# MICROELECTRONIC DEVICES AND CIRCUITS 

2006 Electronic Edition

Clifton G. Fonstad<br>Department of Electrical Engineering and Computer Science<br>Massachusetts Institute of Technology

## Microelectronic Devices and Circuits, 2006 Electronic Edition

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Errata in the original text identified as of August 15, 2006 have been corrected in this edition.
This edition will appear enlarged $110 \%$ from the original page size when printed on standard letter paper ( 8.5 " x 11 ").

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Most books exist because the authors felt that there were no other books that said what they felt needed to be said in the way they wanted to say it. I felt that a different book was needed, too, and this book is my attempt to fill that need. This text is "different" for what it does not include as well as for what it does include, and this uniqueness merits some discussion.

First, this text does span a range of topics from semiconductor physics to device function and modeling to circuit analysis and design. It is a basic premise of this text that it is important in a first course on semiconductor electronics to address this broad range of topics. Only in this way can we adequately emphasize from the beginning the interactions between physics, devices, and circuits in modern integrated system design.

Second, this text does not include, except as an appendix, semiconductor band theory or any of the associated theoretical baggage that implies (e.g., Fermi statistics, effective mass theory, etc.). It is another basic premise of this text that such material is best left for later, specialized courses and is in fact not necessary for a first, thorough treatment; you do not need to understand energy bands to understand $p-n$ junctions, bipolar transistors, and FETs. As a consequence this text can be used by college sophomores who have had only a basic introduction to physics and circuits. More importantly, by teaching no more semiconductor physics than is necessary to understand the devices, this text can place more emphasis on actually developing this understanding.

Third, this text does take as its mission to teach the broader topic of modeling using semiconductor electronics as a vehicle. Therefore it is a text that should be of value to all engineering students. If you learn something about semiconductor electronics, so much the better, but you will certainly gain an appreciation of the issues inherent in developing and applying physical models.

At the same time, this text does not emphasize the use of sophisticated computer models. The focus here is instead on understanding and choosing between various approximate models to select one that might be suitable, for example, for a back-of-the-envelope calculation, estimation, and/or evaluation of a design concept. Computer models have their place and are extremely important for engineers, but in a text at this level they are more dangerous than anything else since they tend to work against developing the insight we seek.

Fifth, this text does include design, as well as analysis. Design is admittedly not a main focus, nor is much time devoted specifically to it, but some design excercises are included, and a design experience is recommended as a complement to any course based on this text. Only through the exercise of design -of, for example, choosing a circuit topology and, given a topology, selecting component values to achieve certain performance goals - can the lessons of this text be truly learned.

Sixth, this text does not attempt to be the final word on any of the topics it addresses. It presents a correct first treatment and imparts a functional level of knowledge, but it is also only preparation for a second tier of specialization, be it in physics, devices, circuits, and/or systems, that surely must follow.

Seventh, this text does contain much more material than can be covered in any one course; yet, eighth, an instructor using this text does not have to use all of this material, nor, in fact, does he or she have to use it in the order it appears in the table of contents. I have attempted to write this text in such a way that it is possible to use many different subsets and orderings of the material, and in such a way that discussions of more advanced modeling and of more specialized and less pervasive devices can be skipped over without loss of continuity. (Please see "Comments on Using This Text" below for more on these points.)

Also, this text does have its roots in a long legacy of semiconductor electronics education at MIT, and none of the preceding litany of do's and don'ts are claimed to be original to this text. In 1960 the Semiconductor Electronics Education Committee (SEEC) was formed under the leadership of MIT faculty members to address the question of undergraduate electrical engineering education in light of the dramatic changes that were then taking place in the field of electronics with the advent of the silicon transistor and integrated-circuit technology. An important product of that effort was an appreciation for the close coupling between semiconductor physics, device modeling, and circuit analysis and for the value of teaching these topics in a coherent unit. The SEEC produced an excellent, very carefully written series of seven paperback volumes and led indirectly to the publication of a textbook: Electronic Principles-Physics, Models, and Circuits by Paul E. Gray and Campbell L. Searle (Wiley, New York, 1969). The present text unashamedly builds upon these SEEC foundations. It addresses a similarly broad range of topics at a similarly accessible level, differing primarily only in that it does so in a way that reflects the field of semiconductor electronics as it exists now over 30 years after SEEC (i.e., in the 1990s).

## COMMENTS ON USING THIS TEXT

As stated earlier, I have attempted to write this text in such a way that it is possible to use many different subsets and orderings of the material, and I have used it to teach the subject 6.012-Electronic Devices and Circuits at MIT following several topic sequences. The order in which the material appears in this text is a relatively traditional one and it works well. It does, however, mean that circuits are discussed only after a considerable amount of time has been spent on physics
and devices. A convenient, timely way to get circuits in sooner is to present the MOSFET before the BJT, and to discuss MOS logic circuits right after finishing the MOSFET. When doing this, I have found that it is useful to follow the text through the reverse biased $p$-n diode (Section 7.2) so the depletion approximation has been introduced, and to then go to Chapters 9,10 , and 15 before returning to Chapter 7 and continuing with Section 7.3.

Chapters 14 and 16 contain material that can also be presented earlier with good effect. One can easily argue that all of the material in these chapters could have been integrated into the earlier device and circuits chapters, but I resisted doing this because I feel it is useful to have the discussions of frequency response collected in one place; the same is true of the switching transients discussions. Having said this, however, I do usually include the discussion of switching times of MOSFET inverters with the discussion of their other characteristics. Another example is the switching transient of a $p-n$ diode, which is a good issue to discuss soon after teaching diode current flow. The fact that there are plenty of carriers to sustain a reverse current immediately after a diode has been switched from forward to reverse bias is easy to see, and it reinforces the students' understanding of current flow in a diode.

Finally, it is important to realize that we are unable to cover all of the material in this text in our one-semester course at MIT. Typically, we wait until a senior-level device elective to cover the more advanced device models; to discuss JFETs and MESFETs, optoelectronic devices, memory, and bipolar logic; and to cover much of the discussion of large signal switching transients. I recommend considering the following topics and sections (section numbers in parentheses) when you are looking for material to delete or de-emphasize: physics issues such as high-level injection solutions (3.2.3) and certain boundary conditions (5.2.3 $\mathrm{c}-\mathrm{e})$; advanced models for diodes (7.4.1b), BJTs (8.2.1b), and MOSFETs (10.1.1b); and certain more specialized or less pervasive devices such as photoconductors (3.3), photodiodes (7.5), LEDs (7.6), phototransistors (8.3), JFETs (10.2), MESFETs (10.3), memory cells (15.4), and charge-coupled devices (16.2.2b). If, on the other hand, you are looking to expand upon, or add to, any of the material in the main text, there is ample material in the appendices presented at much the same level on energy bands, Fermi statistics, and the effective mass picture (Appendix C), on metal-semiconductor junctions (Appendix E), and on processing (Appendix G).

## ACKNOWLEDGMENTS

First and foremost, I thank my wife, Carmenza, and my sons, Nils and Diego, for their support, tolerance, and love throughout this project.

The present text reflects very much the philosophy of the late Professor Richard B. Adler, who had a great influence on me since the day I first set foot on the MIT campus. Many others, including Professors A. C. Smith, R. F. Morgenthaler, D. J. Epstein, and R. H. Kyhl, have also taught me a great deal about this material and how to teach it over the years, and I gratefully acknowledge their influence and impact on me and this text.

I also thank my colleagues at MTT, especially Jesus del Alamo, Dimitri Antoniadis, Jim Chung, Martha Gray, Leslie Kolodziejski, Harry Lee, Marty Schlecht, and Charlie Sodini, who have taught from these notes and/or who have set me straight on various issues, for their many constructive comments and suggestions. Thanks are also due to the many students who have used these notes in classes for their numerous helpful student's-eye-view comments. A particular thank you to Tracy Adams for the many hours she spent going through much of the near-final version. My thanks also to Angela Odoardi, Charmaine Cudjoe-Flanders, Karen Chenausky, and Kelley Donovan for their enormous help translating my scrawl into a presentable manuscript.

In addition, McGraw-Hill and I would like to thank the following reviewers for their many helpful comments and suggestions: Scott E. Beck, formerly of University of Arizona; currently at Air Products in Allentown, PA; Dorthea E. Burke, University of Florida; John D. Cressler, Auburn University; Robert B. Darling, University of Washington; William Eisenstadt, University of Florida; Eugene Fabricus, California Polytechnic Institute; Mohammed Ismail, Ohio State University; J. B. Kreer, Michigan State University; M. A. Littlejohn, North Carolina State University; Gerald Neudeck, Purdue University; and Andrew Robinson, formerly of University of Michigan; currently with Advanced Technology Laboratories in Bothell, WA.

Finally, I welcome further comments, suggestions, or corrections from users of this text; I invite you to communicate with me by electronic mail (fonstad@mtl.mit.edu).

Clifton G. Fonstad

## COMMENTS ON THIS EDITION (8/15/06)

The publication of this 2006 Electronic Edition of Microelectronic Devices and Circuits has been accomplished primarily as a result of the efforts of Professor Ioannis (John) Kymissis of Columbia University, a recent Ph.D. recipient from M.I.T. The author is grateful to John for helping realize this edition.

## MODELING

The title of this text is Microelectronic Devices and Circuits, but it is really a book about modeling. Inevitably, this focus will tend to be neglected as we concentrate on learning how semiconductor diodes and transistors work and how they are used in analog and digital circuits. Thus, it is important that we start with a few comments on models and on our hidden agenda.

### 1.1 GENERAL COMMENTS

You are familiar with models for circuit components-resistors, capacitors, inductors, wires - and you have learned that, for example, the terminal current-voltage relationship of a real resistor that you might get from a stockroom or buy at an electronics store may be represented, or modeled, by an "ideal" resistor for which $v_{R R^{\prime}}=i_{R} R$, where $v_{R R^{\prime}}$ is the voltage difference between the two terminals of the resistor, $i_{R}$ is the current into the positive reference terminal (and out the negative terminal), and $R$ is the resistance of the resistor, in units of ohms $(\Omega)$. We tend to think of this model when we encounter an actual resistor, and the distinction between a real resistor and the model becomes blurred. This is all right as long as we do not lose sight of the fact that $v=i R$ is just a model, and that as such it has limitations. For example, if we change the temperature of a resistor, its $R$ value will change, and at very high current levels, the variation of voltage with current is no longer linear, in part because of internal heating. An important part of learning a model is learning its limitations, and an important part of using a model is remembering that it has limitations and knowing what they are.

In this text, one of our objectives is to develop accurate models with as few limitations as possible. We also want models that are useful. By "useful" we mean models that are analytical and, often, that are easy to use in hand calculations. We
also mean models that are conceptual and through which we can gain insight into problems. Not surprisingly, the two objectives of utility and accuracy are not always consistent, and compromises usually must be made. This often leads to a hierarchy of models for a device, ranging from the very simple and approximate to the very precise and complex. An important part of modeling and analysis is knowing which model to use when.

The real value of a good model is that it lets us predict performance. It lets us improve, modify, and apply; it lets us design new things, not just analyze old ones; and it provides a high degree of confidence that what we design will work. The most successful models are founded on an understanding of the physical processes at work in what is being modeled. Such models are conducive to the development of physical insight, and they are essential for predicting the unknown.

To illustrate the importance of understanding the physics of a process in order to develop useful models for it, we can look at two examples where the physics is not yet understood, and thus for which models capable of predicting performance do not exist: high-temperature superconductivity and cold fusion. In the first instance, people ask, "Can we make a room-temperature superconductor? If not room temperature, how high?" We cannot even pretend to answer these questions without understanding the basic mechanism behind the lack of resistance in the new "high-temperature" superconductors. The same is true for cold fusion. We cannot predict whether test-tube fusion will be a useful source of energy, nor can we begin to improve upon the minuscule amounts of energy produced thus far without understanding the physics of the phenomenon, that is, without a model for it.

As a final example, let us look at models for our planet and at how those models evolved. Hundreds of years ago, many fairly isolated civilizations existed, all of which had developed models for the universe. In the Western European civilization there were two competing models: the flat-earth model and the round-earth model. There was also a great deal of interest among businessmen in developing trade with the Chinese, Indian, and other Far Eastern civilizations; and depending on which model of the earth you believed in, you saw different possibilities for getting to the Far East. According to both models, you could go directly east over land, but that was known to be both dangerous and difficult. Both models also indicated that you might be able to sail along the coast of Africa, but this journey was also very dangerous. The round-earth model suggested a third route, namely, west. According to the model subscribed to by Columbus, sailing due west would be a long, but practical, way of getting to the Far East.

On the one hand, the model Columbus used, which was based on a better physical understanding of the solar system, was the more correct; it gave him the confidence to sail west from Spain without fear of sailing off the edge of the earth into an abyss. On the other hand, the model had some serious flaws and needed to be modified. For one thing, the model didn't include North and South America, but that was not a fatal flaw. More important for Columbus, his model didn't use the right diameter for the earth, so he thought the Far East would be a lot closer than it was. At that time many scientists thought the earth was bigger than Columbus did; and, ironically, if Columbus
had believed the big-earth advocates (who were right, after all), he might not have even tried to sail west, since he could not have carried all of the provisions needed on the ships then available. The colonization of America might have been delayed a few years, but bigger boats and a belief in the round-earth model would eventually have led someone to sail west.

Today we know that the earth is round and we know how big it is, but how often do we use the round-earth model in daily life? For most of what we do, a flatearth model is perfectly adequate and much easier to work with. Mathematically, we recognize that the flat-earth model is a linear approximation to the round-earth model, valid for motion in our immediate vicinity. In circuit jargon, we would call it a small-signal, or incremental, linear equivalent model for the earth.

There are many different models for the earth, ranging from a flat slab to an infinitesimal point, and each has utility in the right situation. One of the important things to learn about modeling is how to trade off complexity and accuracy, and how to choose the appropriate model for the task at hand.

### 1.2 EMPIRICAL DEVICE MODELS

Consider the bipolar transistor. You are familiar with its terminal characteristics, shown in Fig 1.1, and with the large-signal and incremental models for the bipolar transistor, shown in Fig 1.2. You might legitimately ask, "Don't I know enough? Why do I need to bother with a lot of physics and spend an entire semester learning more about transistor models?"

The problem is that so far these models are only empirical. We got the large-signal model by measuring a device's characteristics and then mathematically fitting those measured characteristics to an ad hoc collection of ideal circuit components - model building blocks, if you will-that give the same behavior of terminal currents and voltages. In general, more than one combination of components will give the same terminal characteristics, but experience with several devices and a little common sense helps us select a model topology that doesn't


FIGURE 1.1
Input (a) and output (b) families of terminal characteristics for an npn bipolar junction transistor (BJT).


FIGURE 1.2
Large-signal (a) and incremental (b) circuit models for the terminal characteristics of an apn bipolar junction transistor.
change dramatically from device to device, a topology that somehow "fits" the bipolar transistor. We may develop confidence that our model is "right" for the bipolar transistor, but it is purely empirical, with only a fortuitous connection at best to the internal workings of the device. Based on this model, we have no way of knowing if, for example, there is any way of changing the diode breakpoint values of 0.6 V and 0.4 V . We don't know what determines $\beta$ and how it can be changed, what happens if the temperature is raised or lowered, or whether the device will work at 1 GHz or with 100 A of collector current. We don't even know whether we have to ask such questions or if there are other, more important questions we should be asking. With empirical modeling, what you've seen is what you've got, and if you want to try something new, you have to take some new measurements.

We want to go beyond empirical modeling to develop models based on the physics of devices so that we can answer such questions with some generality and confidence, before doing extensive measurements. More important, we want models that will let us predict the unknown.

### 1.3 WHY SEMICONDUCTORS? WHY TRANSISTORS?

The need to learn modeling should now be clear to you, but the choice of semiconductor transistors as the context in which to study modeling may not be. Today electronic system design has very much become integrated circuit design. Thus, whereas at one time an engineer could specialize either in devices or in circuits or in systems, it is now impossible to separate systems from the semiconductors
used to realize them. Now more than ever it is essential that engineers dealing with electronic devices, circuits, or systems at any level have the basic familiarity with semiconductors and transistors that this text provides.

In addition, there is an elegance in the modeling of semiconductor transistors and in the hierarchy of models that exists for them that makes this a very satisfying subject to learn. Many students actually end up enjoying this material.

## CHAPTER 2

## UNIFORM SEMICONDUCTORS IN EQUILIBRIUM

We begin our exploration of semiconductors with a discussion of thermal equilibrium, a concept that is very important to understand and very powerful to use. We will then look at semiconductors in thermal equilibrium and discuss how to modify their charge carrier populations in useful ways.

### 2.1 THERMAL EQUILIBRIUM

Thermal equilibrium is not easy to define in precise language, and a course in thermodynamics is really needed to quantify the concept, but our purposes require no more than basic understanding. The following description should help you develop an intuitive feel for the concept of thermal equilibrium.

When we speak of an object being "in thermal equilibrium with its surroundings," we mean that it has the same temperature as its surroundings (which must, in turn, all be at one temperature) and, furthermore, that it is completely free of external stimulation. It is not being heated or cooled, it is not being illuminated, it is not being influenced by an electric or magnetic field, and it is not being pushed by the wind. It gives as much energy to every object with which it interacts as it receives from that object, and there is no net change in its condition over time. It just is.

## Example

Question. Consider a bucket of water sitting with you on the floor in a closed room. Assume the room is at a comfortable $291 \mathrm{~K}\left(18^{\circ} \mathrm{C}\right.$ or $\left.65^{\circ} \mathrm{F}\right)$, and the water and bucket are also at 291 K . Is the water in thermal equilibrium?

Discussion. If the lights are on or if there is light coming in through an open window, the bucket is not in thermal equilibrium because the light source is at a much higher temperature than $18^{\circ} \mathrm{C}$, and the water is being warmed by that light. The water may well be losing heat to the room, which is in turn losing heat to the outside, and the temperature of the whole ensemble may remain essentially constant, but the water is not in thermal equilibrium.

What if you cover the windows and turn out the lights? That is a big improvement but you are still in the room. You are hotter than $18^{\circ} \mathrm{C}$, and you are a source of energy that is heating the water.

What if you leave the room? Can we now assume that the bucket is in thermal equilibrium? Probably, but be careful. It sounds like nothing is happening, but in fact the water, bucket, and surroundings are all seething with activity. The atoms and molecules that make up these materials are all vibrating rapidly. Still, that is no reason to say that the bucket of water is not in thermal equilibrium. This motion is, after all, what is involved in being at a finite temperature. An object in thermal equilibrium with its surroundings is not changing with time in a global or average sense, but that is not inconsistent with motion of individual, indistinguishable atoms, electrons, or bonds. There must simply be no net motion of any of these particles.

If you were to check on the bucket of water a month later, you would find that most of the water had evaporated from the bucket. Some would be in the air (i.e., it would be more humid in the room), some would be adsorbed on surfaces of the room or absorbed in them (depending on what they were made of), and some might be on the floor. Clearly, the water and bucket were not in thermal equilibrium in an absolute sense when you left the room a month earlier. Are they now? The answer really depends on the room and, more important, on how strictly thermal equilibrium is defined. It will never be in absolute thermal equilibrium-not in your lifetime, anyway - but it may be close enough.

The important lesson to be learned here about modeling is that every model has limitations, and none is perfect, but all you really need is one that is close enough for the task at hand. For the example of the bucket of water, we should have been asking not "Is it in thermal equilibrium?" but rather "Can it be modeled as being in thermal equilibrium?" And to answer that question, we have to know why we are modeling the bucket of water in the first place. For some applications, the fact that the bucket was illuminated and someone was in the room with it would be insignificant, and treating it as if it were in thermal equilibrium would be entirely satisfactory. In others-say, an experiment that took two years-it may never be possible to assume that it is in thermal equilibrium.

To summarize, we say that an object is in thermal equilibrium if it is "free" of all external stimulation. Recognizing that an object will always have surroundings and that its having a finite temperature means that its constituent atoms are in constant random motion, we understand that no practical object can ever be in strict thermal equilibrium, yet we also understand that in many instances an object will be close enough.

To progress further, we need to understand more about the reason for having a concept of thermal equilibrium. The answer is that thermal equilibrium is useful as a reference point, a baseline. It represents a condition we can define and use as a starting point for modeling what happens to semiconductors when we apply external stimulations. That is what we really care about, of course: semiconductors that
have been shaped into devices and that have voltages applied, currents flowing, heat and light exciting them-and that are doing something useful. They certainly are not in thermal equilibrium, but to understand them we first have to understand semiconductors in thermal equilibrium.

### 2.2 INTRINSIC SILICON

One of the simplest semiconductors, and by far the most important, is singlecrystal silicon, Si. Silicon is element 14 in the periodic table and has four outer bonding electrons. It forms a covalent crystal in which each atom shares its four outer electrons with its four nearest neighbors. Physically, each silicon atom in a silicon crystal is at the center of a tetrahedron of four other silicon atoms; this arrangement is illustrated in Fig. 2.1. The extended crystal structure arising from this local arrangement is illustrated in Fig. 2.2. It consists of two interwoven face-centered cubic lattices, or crystal structures, one of which is shifted a quarter of the way along the cube diagonal with respect to the other lattice. To help you see this, a single face-centered cubic lattice is illustrated in Fig. 2.3a, and in Fig. $2.3 b$ the two sublattices forming the silicon lattice are shown. The arrows in Fig. $2.3 b$ are provided to help you visualize the quarter shift; notice that although the arrows show a shift along one particular body diagonal, the structure can just as well be viewed as having been formed by a shift along either of the two other body diagonals. The crystal in Fig. 2.2 is called the diamond lattice, because this structure was originally identified as the form of crystalline carbon called diamond.


FIGURE 2.1
Representative silicon atom with its four nearest neighbors. The circles represent the atoms, the solid lines indicate covalent bonds, and the dashed lines outline the tetrahedral shape.


FIGURE 2.2
The unit cell of the diamond lattice. This cell repeated in all directions forms the extended silicon crystal. The unit cell is approximately $5.43 \AA$ on a side in silicon (see App. A for data on other semiconductors), and there are roughly $5 \times 10^{22} \mathrm{Si}$ atoms per cubic centimeter.

Drawing three-dimensional pictures of a silicon lattice can be difficult, tedious, and confusing, so we often use a flat representation, as illustrated in Fig. 2.4, realizing full well that this model does not display the spatial arrangement of the atoms. It is, however, perfectly adequate for counting and locating the electrons. In the flat model of the silicon lattice in Fig. 2.4, the circles represent the Si nucleus and the inner two shells of 10 electrons (the "ion core"). It thus has a net charge of $+4 q$, where $q$ is $1.6 \times 10^{-19} \mathrm{C}$. The lines in Fig. 2.4 each represent one bonding electron in a covalent bond between two Si atoms. These electrons each have a charge of $-\dot{q}$, and the entire structure is electrically neutral. In a perfect silicon crystal in thermal equilibrium at 0 K (i.e., at absolute zero temperature), all of the electrons either are in one of the inner atomic energy levels or are participating in the bonding. No electrons are free to move about the crystal, and the material is insulating.

An important property of semiconductors is that electrons can be removed from the covalent bonds by supplying sufficient energy and can thus be "freed" to move about within the crystal. Once an electron can move about the crystal, it can


FIGURE 2.3
(a) The unit cell of the face-centered cubic crystal structure. (b) The unit cell of the diamond structure, showing the two interwoven face-centered cubic sublattices. In the diamond structure both sublattices are composed of the same atomic species; if the sublattices are composed of different elements, this is called the zinc-blend structure. Note that only the atoms of the second sublattice (black atoms) falling within the unit cell of the first sublatice (white atoms) are shown.


FIGURE 2.4
A two-dimensional representation of the diamond lattice. Each line represents a shared electron in a covalent bond. Each circle represents a nucleus with its inner two shells of electrons.
carry electric charge from one place to another-that is, it can produce currentand this is very much of interest to electrical engineers, as well as others.

In a useful semiconductor, it takes a substantial amount of energy to free an electron from a bond. By "substantial" we mean much more energy than is available from the normal thermal motion of the ion cores in the crystal. This latter energy is on the order of $k T$, where $k$ is Boltzmann's constant, $8.62 \times 10^{-5}$ $\mathrm{eV} / \mathrm{K}$, and $T$ is temperature. At room temperature, $k T$ is approximately 0.025 eV or, $1 / 40 \mathrm{eV}$. (This is an important number to remember, as you will use it repeatedly when working with semiconductor devices.)

In silicon it takes a minimum of 1.124 eV of energy to "free" an electron from a bond so that it can move about the crystal and conduct (i.e., carry current). To visualize this, refer to Fig. 2.5, where the number of allowed energy locations or levels for electrons is plotted as a function of the energy of the electrons occupying them. The electrons in the covalent bonds are in a set of energies called the valence band. The inner-core-level electrons are at still lower energies (not shown in the figure). Electrons free to conduct are in a set of energy levels called the conduction band. They are at a higher energy and separated from the valence band by 1.124 eV in Si . This separation is called the energy gap, or bandgap, and designated $\Delta E_{g}$. (For a more thorough, quantitative discussion of the band model, refer to App. C, Sec. C.1.)

At a temperature greater than absolute zero, the electrons in bonds continually exchange energy with the ion cores (nuclei and their inner electron shells) of the crystal lattice, which are vibrating with their thermal energy. That is, after all, what it means for the crystal to be at a temperature greater than absolute zero; it means that we have put energy, thermal energy, into the crystal. The energy of an average ion or electron in the crystal is on the order of $k T$, but some have much less energy and some much more. In fact, a small fraction of the electrons acquire enough energy through collisions with other electrons and ions to move from the valence band to the conduction band.


FIGURE 2.5
Schematic plot of the density of states available to electrons about the energy gap of a semiconductor as a function of electron energy.

At the same time that some electrons are getting enough energy to be freed from their bonds, other electrons already in the conduction band suffer collisions, giving up their extra energy and falling back into an empty bond. The process is a very dynamic one, with bonds continually being broken and reformed, even though the crystal is in thermal equilibrium. Over a period of time the average number of electrons in the conduction band depends on the temperature and on the size of the energy gap. In intrinsic silicon at room temperature an average of $1.08 \times 10^{10}$ electrons per cubic centimeter are in the conduction band. This sounds like a large number, until one realizes that there are over $10^{22}$ electrons per cubic centimeter in bonds. Thus, only one in a trillion ( $10^{12}$ ) of the outer electrons have gotten enough energy to move from the valence to conduction band. Electrically, as we shall see in Chap. 3, the crystal is still effectively an insulator.

Thus far we have focused on the electrons, but in semiconductors it is equally important to look at the empty bonds left when an electron is excited up to the conduction band. The electron has a negative charge of $-q$, where $q$ is $1.6 \times 10^{-19} \mathrm{C}$, so that removing an electron from a previously neutral bond leaves an empty bond that has associated with it a positive charge of $+q$. The interesting thing is that the empty bond can also move about the crystal and transport electricity. An electron in a neighboring bond can move over into the empty bond with little or no additional energy, as illustrated in Fig. 2.6. The empty bond is thus effectively "moved" over to the position of the neighboring bond. It is an electron that has moved, but it is much easier to keep track of the empty bond, since there are so few of them, than to keep track of the

(a)

(b)

FIGURE 2.6
(a) The formation of a hole-electron pair through excitation of an electron from a valence bond to a conducting state. (b) The motion of a hole through the change in location of an unfilled valence bond.
bonding electrons. As the empty bond moves, the net positive charge associated with it also moves. Amazingly, this empty bond, which we call a hole, can be modeled very nicely as a particle itself, a particle similar to an electron but with a positive mass and a positive charge, $+q$ (see App. C, Sec. C.2).

Thus, when an electron is excited from the valence band to the conduction band, two particles that can carry electrical current are "created." One is a conduction electron, which we will generally call just an electron, and the other is a hole. We will denote the concentration of electrons per cubic centimeter as $n$ and the concentration of holes as $p$. We will add the subscript $o$ to these symbols to denote their values in thermal equilibrium. Thus, $n_{o}$ and $p_{o}$ are the thermal equilibrium concentrations of electrons and holes, respectively. The unit we will use for concentrations is $\mathrm{cm}^{-3}$.

In a perfect crystal of pure silicon, electrons and holes can only be created in pairs, since for every electron freed there is an empty bond left behind, and their concentrations are equal (i.e., $n_{o}=p_{o}$ ). Such a perfect, pure crystal is called intrinsic, and the carrier concentrations in an intrinsic semiconductor are equal to what is called the intrinsic carrier concentration, denoted by $n_{i}$. As already indicated, $n_{i}$ in silicon at room temperature is $1.08 \times 10^{10} \mathrm{~cm}^{-3}$. The intrinsic carrier concentration is a very sensitive, exponential function of temperature, and thus it is very important to state the temperature. Unless otherwise specified, we will be concerned with operation at room temperature, or roughly 300 K .

To summarize, in an intrinsic semiconductor,

$$
\begin{equation*}
n_{0}=p_{0}=n_{i}(T) \tag{2.1}
\end{equation*}
$$

### 2.3 EXTRINSIC SILICON

Intrinsic silicon is highly resistive, and silicon would be relatively uninteresting if we could not do more with it. Fortunately, we can do a great deal more with it through the controlled addition of impurities, which allow us to vary significantly and predictably the thermal equilibrium concentrations of holes and electrons. These very special impurities are given the special name dopants and can be either donors or acceptors. We will first look at how dopants work in silicon, and then will learn how to calculate $n_{o}$ and $p_{o}$ in silicon samples for which we know the dopant concentrations.

### 2.3.1 Donors and Acceptors

Silicon is in column IV of the periodic table and, as we have said, has four outer-shell electrons per atom. In the diamond lattice, each Si atom shares its four outer electrons with the four nearest neighbors in four covalent bonds. If we could replace one silicon atom with an atom from column V of the periodic table, that atom would have one more outer electron than is needed for bonding. This situation is illustrated schematically in Fig. 2.7a. This atom also has one more positive charge on its nucleus than does Si , so the dopant atom is electrically neutral overall, but it is the presence of the "extra" outer electron that is important to us. It is not a priori obvious that an arbitrary atom from column V can be put into the silicon lattice in this manner, but it turns out that phosphorous $(\mathrm{P})$,


FIGURE 2.7
(a) An antimony donor atom substitutionally located in a silicon lattice electron. (b) The location on an electron energy scale of the fifth electron on a donor atom.
arsenic (As), and antimony ( Sb ) atoms can be substituted for silicon atoms in a Si crystal; nitrogen ( N ) atoms, on the other hand, cannot.

The next question is where on the energy scale the extra electron associated with a substitutional column V dopant lies. It turns out for $\mathrm{P}, \mathrm{As}$, and Sb dopant atoms that the electron's energy is approximately 50 meV below the bottom edge of the conduction band. This is illustrated in Fig. 2.7b. If this electron gets just 50 meV of additional energy, perhaps from vibrations of the crystal lattice, it can be excited to the conduction band and freed to move about the crystal; it is then indistinguishable from any other conduction electron. Notice an important difference, however, from the situation where a conduction electron is created by breaking a covalent bond. In that situation a mobile electron and a mobile hole are created. Now a mobile electron is created, but the positive charge associated with the column V ion is fixed in place; it cannot move.

Elements that can be put substitutionally into a semiconductor lattice and that then have electrons at energies where they can be easily excited into the conduction band are called donors. The energy needed is called the donor ionization energy $E_{d}$, and a donor whose electron has been excited into the conduction band is said to be ionized. It has a net charge of $+q$. Donors of practical interest in silicon, such as P , As, and Sb , are termed shallow donors. They have ionization energies sufficiently low that, at concentrations of interest in devices, they will be ionized at room temperature. That is to say, if a silicon crystal contains $N_{d}$ shallow donor atoms per cubic centimeter, then almost all will be ionized at room temperature, and the density of ionized donor ions, $N_{d}^{+}$, will be essentially $N_{d}$ :

$$
\begin{equation*}
N_{d}^{+} \approx N_{d} \tag{2.2}
\end{equation*}
$$

Logically, the next question is what are $n_{o}$ and $p_{o}$, the thermal equilibrium hole and electron concentrations, in a silicon crystal doped with a known concentration of donors, $N_{d}$. We cannot answer this question yet, but because each conduction electron came either from a donor or from a valence bond, we can say that the concentration of mobile electrons, $n_{o}$, must equal the concentration of holes, $p_{o}$, plus the concentration of ionized donors:

$$
\begin{equation*}
n_{o}=p_{o}+N_{d}^{+} \tag{2.3}
\end{equation*}
$$

Using Eq. (2.2), we also know that

$$
\begin{equation*}
n_{0} \approx p_{0}+N_{d} \tag{2.4}
\end{equation*}
$$

Before proceeding with the determination of $n_{o}$ and $p_{o}$, let us consider what would happen if instead of putting impurities from column V into the Si crystal, we put in impurities from column III. A column III atom-boron, for instance-has only three outer electrons; thus, although it will be electrically neutral if put substitutionally into a silicon lattice, it will not be able to fill one of the four covalent bonds it is expected to make with its four nearest neighbors (see Fig. 2.8a). What happens is perhaps more difficult to visualize than the case for a donor, but the situation is analogous, and in this case it is a mobile hole that can be readily created. The column III dopant introduces a new energy level
for electrons just above the valence band, as pictured in Fig. 2.8b. An electron in a covalent bond that gets enough energy, about 50 meV in the case of boron in silicon, can form the missing bond of the dopant. That electron is now located spatially in the vicinity of the dopant atom, and a hole is created that can move about the crystal. In this case the dopant is called an acceptor, and it is said to be ionized. The energy the electron had to acquire is the acceptor ionization energy, $E_{a}$, and the ionized acceptor has a net charge of $-q$ associated with it.

Useful acceptors are shallow and have ionization energies small enough that at room temperature all of them will be ionized. Thus, if the shallow acceptor concentration is $N_{a}$, we have

$$
\begin{equation*}
N_{a}^{-} \approx N_{a} \tag{2.5}
\end{equation*}
$$

In silicon, the most useful acceptor dopant is boron (B). Of the other possibilities, indium ( In ) is not good because its ionization energy is too large, aluminum ( Al ) is not good because it oxidizes too readily and is difficult to work with as a dopant, and gallium $(\mathrm{Ga})$ is too hard to introduce into silicon in a controlled way.

As was the case with donors, we cannot yet say what $n_{0}$ and $p_{o}$ are given $N_{a}$, but we can get one equation relating these two unknowns:

$$
\begin{equation*}
n_{o}+N_{a}^{-}=p_{o} \tag{2.6}
\end{equation*}
$$

Using Eq. (2.5), we have

$$
\begin{equation*}
n_{0}+N_{a} \approx p_{0} \tag{2.7}
\end{equation*}
$$




FIGURE 2.8
(a) A boron acceptor atom substitutionally located in a silicon lattice with its unfilled bond, or hole. (b) The location on the electron energy scale of the unfilled bonding electron sites.

In a crystal with both donor and acceptor atoms present, we can do the same bookkeeping or charge concentration accounting. The total number of electrons in the conduction band, $n_{o}$, and on ionized acceptors, $N_{a}^{-}$, must equal the number of empty bonds (i.e., holes), $p_{o}$ plus the number of ionized donors, $N_{d}^{+}$:

$$
\begin{equation*}
n_{o}+N_{a}^{-}=p_{o}+N_{d}^{+} \tag{2.8}
\end{equation*}
$$

Unless otherwise specified, we can assume that the donors and acceptors are shallow and completely ionized. Thus, using Eqs. (2.2) and (2.5),

$$
\begin{equation*}
n_{o}+N_{a} \approx p_{o}+N_{d} \tag{2.9}
\end{equation*}
$$

This can also be written as

$$
\begin{equation*}
n_{o}-p_{o} \approx N_{d}-N_{a} \tag{2.10}
\end{equation*}
$$

We define $N_{d}-N_{a}$ as the net donor concentration $N_{D}$. At times it is convenient to also define a net acceptor concentration $N_{A}$, as $N_{a}-N_{d}$. Thus,

$$
\begin{equation*}
N_{D} \equiv N_{d}-N_{a} \tag{2.11}
\end{equation*}
$$

and

$$
\begin{equation*}
N_{A} \equiv N_{a}-N_{d} \tag{2.12}
\end{equation*}
$$

### 2.3.2 Detailed Balance

We are trying to find $n_{o}$ and $p_{o}$ in a crystal of silicon for which we know $N_{d}$ and $N_{a}$, and thus far we have one equation, Eq. (2.10). We need another equation. To get it, we need to understand the principle of detailed balance and what this principle means for holes and electrons in semiconductors.

To proceed we will look in even more detail at what is happening inside a doped, or "extrinsic," silicon crystal in thermal equilibrium. We have mentioned several times that a crystal in thermal equilibrium is seething with activity. The constituent atoms are vibrating about their nominal locations within the crystal; pairs of holes and electrons are continually being created as bonds are being broken and simultaneously electrons and holes are combining to reform covalent bonds; and the conduction electrons and holes are moving randomly about the crystal. There is no net motion of charge, and there is no net change in $n_{0}$ or $p_{o}$, but microscopically there is continual motion and continual change. A very dynamic equilibrium exists.

Look for a moment at the carrier generation processes. We can think of three processes that might be occurring, and we can represent them using a notation familiar from chemistry:

$$
\begin{aligned}
\text { Completed bond } & \leftrightarrows \text { Hole }+ \text { Electron } \\
\text { Neutral donor } & \leftrightarrows \text { Ionized donor }+ \text { Electron } \\
\text { Neutral acceptor } & \leftrightarrows \text { Ionized acceptor }+ \text { Hole }
\end{aligned}
$$

Focus now on the first process, hole-electron pair generation and recombination, and consider what more we might be able to say about it. Begin with the generation process,

$$
\text { Covalent bond } \rightarrow \text { Hole }+ \text { Electron }
$$

and define a generation rate $G(T)$, which is the rate, in number per cubic centimeter per second $\left(\mathrm{cm}^{-3} \cdot \mathrm{~s}^{-1}\right)$, at which electrons are being excited from covalent bonds to the conduction band, that is, the rate at which hole-electron pairs are being created. We expect $G$ to be a function of temperature.

Although we have mentioned only energy from lattice vibrations as the source of the approximately 1.1 eV needed in Si to create a hole-electron pair, there are many other ways this energy can be acquired. Some are intrinsic, involving just the silicon lattice; some are extrinsic and involve impurities or defects in the crystal; and some are external, involving external stimulation. (Clearly, these external processes must not be present in thermal equilibrium.)

Consider some possible intrinsic processes. One is generation due solely to thermal energy in the lattice (i.e., vibrations), and we can denote this as $G_{\mathrm{th}}(T)$. Another involves absorption of optical energy, $G_{\text {op }}(T)$. You may not be used to thinking of objects at room temperature as emitting light, but just as a red-hot object glows visibly, objects at room temperature are glowing - that is, radiating albeit very weakly and primarily too far into the infrared region for us to see their radiation. Still, there are some quanta of light (photons) that are energetic enough to excite electrons from the valence band to the conduction band.

Still other generation paths might involve a combination of lattice vibrations (we call them phonons) and light quanta (photons). Generation might be caused by one phonon and one photon, $G_{c 1}(T)$; by two phonons and one photon, $G_{c 2}(T)$; or by $i$ phonons and one photon, $G_{c i}(T)$.

The total generation rate $G(T)$ is the sum of all of these and any other intrinsic generation rates, the extrinsic generation rates, and the external generation rates:

$$
\begin{align*}
G(T)= & G_{\mathrm{th}}(T)+G_{\mathrm{op}}(T)+\sum G_{i}(T)+\sum G_{\text {other intrinsic }}  \tag{2.13}\\
& +\sum G_{\text {extrinsic }}+\sum G_{\text {external }}
\end{align*}
$$

For each of these generation mechanisms there is a corresponding recombination mechanism. Defining $R(T)$ as the recombination rate $\left(\mathrm{cm}^{-3} \cdot \mathrm{~s}^{-1}\right)$, we can immediately write

$$
\begin{align*}
R(T)= & R_{\mathrm{th}}(T)+R_{\mathrm{op}}(T)+\sum_{i} R_{c i}(T)+\sum R_{\text {other intrinsic }}  \tag{2.14}\\
& +\sum R_{\text {extrinsic }}+\sum R_{\text {external }}
\end{align*}
$$

For example, $R_{\mathrm{th}}(T)$ is the rate of recombination with all of the energy involved being given to the lattice as thermal energy, (i.e., phonons), $R_{\text {op }}(T)$ is recombination where the energy is released as a quantum of light (i.e., a photon), and so on.

Next we want to consider how we can relate $G$ and $R$ to the carrier populations, $n$ and $p$.

For generation we argue that $G$ will be independent of $n$ and $p$ as long as there are plenty of covalent bonds left to break and lots of room in the conduction band for electrons to go. That is, we restrict ourselves to situations where the density of broken bonds, $p$, is much smaller than the total density of bonds, roughly $10^{22} \mathrm{~cm}^{-3}$, and where the density of conduction electrons, $n$, is much smaller than the total number of conduction sites, again roughly $10^{22} \mathrm{~cm}^{-3}$. In this case $G(T)$ is not a function of $n$ and $p$.
$R$, on the other hand, must depend on $n$ and $p$ because, clearly, we must have at least one hole and one electron for recombination to occur. Thus, we must have at least $R(T, n, p)$. But we can say more. For $n$ and $p$ small, we must have

$$
\begin{equation*}
R(T, n, p)=r(T) n p \tag{2.15}
\end{equation*}
$$

One way to understand this is to think of forming a Taylor's series expansion of $R(T, n, p)$ in terms of $n$ and $p$. We would have

$$
\begin{align*}
R(T, n, p)= & A+B n+C p+D n^{2}+E p^{2}+F n p+G n^{3}  \tag{2.16}\\
& +H p^{3}+I n^{2} p+J n p^{2}+\text { still higher-order terms }
\end{align*}
$$

All of the coefficients of terms not involving both $n$ and $p$ (i.e., $A, B, C, D, E$, $G, H$, etc.) must be zero because $R$ must be zero if either $n$ or $p$ is zero. The first nonzero term is the second-order term, Fnp. If $n$ and $p$ are sufficiently small, we can stop the expansion there and ignore $I n^{2} p, J n p^{2}$, and all higher-order terms. This gives us Eq. (2.15).

Next we restrict ourselves to thermal equilibrium and to finding $n_{o}$ and $p_{o}$. In thermal equilibrium there will be no net change in $p_{o}$ and $n_{o}$ with time, so generation must equal recombination, that is,

$$
\begin{equation*}
G_{o}(T)=R_{o}(T)=n_{o} p_{o} r(T) \tag{2.17}
\end{equation*}
$$

Note that we have added a subscript $o$ to denote thermal equilibrium.
Equation (2.17) says that the total generation equals the total recombination, but by the principle of detailed balance we can say even more. This principle states that each individual recombination and generation process must balance. That is,

$$
\begin{align*}
G_{\mathrm{th}} & =R_{\mathrm{th}}=n_{o} p_{o} r_{\mathrm{th}} \\
G_{\mathrm{op}} & =R_{\mathrm{op}}=n_{o} p_{o} r_{\mathrm{op}}  \tag{2.18}\\
G_{c i} & =R_{c i}=n_{o} p_{o} r_{c i}
\end{align*}
$$

and so on. If this were not true, some pretty nonsensical things might happen. Suppose, for example, that we had a sample in which every process was balanced except for the intrinsic optical process and the intrinsic thermal process:

$$
\begin{equation*}
G_{\mathrm{th}}+G_{\mathrm{op}}+\sum_{\text {other }} G=R_{\mathrm{th}}+R_{\mathrm{op}}+\sum_{\text {other }} R \tag{2.19}
\end{equation*}
$$

with $\sum_{\text {other }} G=\sum_{\text {other }} R$, but $G_{\text {th }} \neq R_{\text {th }}$ and $G_{\text {op }} \neq R_{\text {op }}$. We are left with

$$
\begin{equation*}
G_{\mathrm{th}}+G_{\mathrm{op}}=R_{\mathrm{th}}+R_{\mathrm{op}} \tag{2.20}
\end{equation*}
$$

Suppose for the sake of discussion that $G_{\text {op }}>R_{\text {op }}$, and that, as must then also be true, $G_{\mathrm{th}}<R_{\mathrm{th}}$. This implies that more optical energy is being absorbed by the sample than is being emitted, while more thermal energy is being given to the crystal lattice than is being absorbed from it. Thus, the sample absorbs optical energy from its surroundings and heats up. This is nonsense if the sample is supposed to be in thermal equilibrium with its surroundings. We conclude that the only way we can avoid inconsistencies such as this is to insist on detailed balance of all of the processes. Clearly, we must have $G_{\mathrm{th}}=R_{\mathrm{th}}, G_{\mathrm{op}}=R_{\mathrm{op}}, G_{c i}=R_{c i}$, and so forth in thermal equilibrium.

This is the result we need to find $n_{0}$ and $p_{0}$. There are many generationrecombination processes that do not involve donors and acceptors and thus do not change with the addition of dopants. For such processes, $G_{j}(T)$ and $r_{j}(T)$ are unchanged by the addition of dopants, and we will have

$$
\begin{equation*}
G_{j}(T)=n_{o} p_{o} r_{j}(T) \tag{2.21}
\end{equation*}
$$

We argued earlier, however, that adding dopants changed $n_{o}$ and $p_{0}$. What we see now is that they may change, but their product must not. At a given temperature, the product $n_{o} p_{o}$ must be independent of $N_{a}$ and $N_{d}$.

Another way to see that the product $n_{o} p_{o}$ must be independent of doping is to think of the process of hole-electron pair generation and recombination as a chemical reaction:

$$
\text { Complete bond } \rightleftarrows \text { Hole }+ \text { Electron }
$$

and use the law of mass action, which says that in equilibrium

$$
\frac{[\text { Hole }][\text { Electron }]}{[\text { Completed bond }]}=K(T)
$$

where the brackets indicate concentration and $K(T)$ is the mass action constant. The hole concentration is $p_{0}$, and the electron concentration is $n_{0}$. Thus, we have

$$
p_{o} n_{o}=K(T)[\text { Completed bond }]
$$

and we see again that the product $n_{o} p_{o}$ is independent of doping (i.e., of the individual values of $n_{0}$ and $p_{o}$ ), as long as the concentration of completed covalent bonds is not reduced noticeably.

To evaluate $n_{o} p_{o}$, recall that we know what $n_{o}$ and $p_{o}$ are in one special case, namely, in intrinsic silicon. In intrinsic silicon, $n_{0}=p_{o}=n_{i}$. Clearly, then, in this case and in general,

$$
\begin{equation*}
n_{o} p_{o}=n_{i}^{2}(T) \tag{2.22}
\end{equation*}
$$

This is our second equation relating $n_{0}$ and $p_{0}$. It is valid as long as $n_{o}$ and $p_{o}$ are much smaller than $10^{22} \mathrm{~cm}^{-3}$. A safe limit is $10^{19} \mathrm{~cm}^{-3}$ in silicon.

### 2.3.3 Equilibrium Carrier Concentration

By combining Eqs. (2.10) and (2.22) we obtain a quadratic equation. Assuming for the moment that $N_{d}$ is greater than $N_{a}$, so that we have $\left(N_{d}-N_{a}\right) \equiv N_{D}>0$, we find that solving the quadratic equation yields

$$
\begin{equation*}
n_{o}=\frac{N_{D}}{2}+\frac{N_{D}}{2} \sqrt{1+\frac{4 n_{i}^{2}}{N_{D}^{2}}} \tag{2.23}
\end{equation*}
$$

and

$$
\begin{equation*}
p_{o}=-\frac{N_{D}}{2}+\frac{N_{D}}{2} \sqrt{1+\frac{4 n_{i}^{2}}{N_{D}^{2}}} \tag{2.24}
\end{equation*}
$$

As a practical matter, it will almost always be the case that $N_{D} \gg n_{i}$, in which case these expressions can be simplified to

$$
\begin{equation*}
n_{o} \approx N_{D}+\frac{n_{i}^{2}}{N_{D}} \approx N_{D} \tag{2.25}
\end{equation*}
$$

and

$$
\begin{equation*}
p_{0}=\frac{n_{i}^{2}}{n_{0}} \approx \frac{n_{i}^{2}}{N_{D}} \tag{2.26}
\end{equation*}
$$

Looking at this result we see that $n_{o}$ is indeed greatly increased over its value in intrinsic material, whereas $p_{o}$ is suppressed correspondingly. The mobile carriers are thus predominantly electrons, and we say that the sample is an extrinsic n-type semiconductor. The electrons are called the majority carriers, and the holes are called the minority carriers in an $n$-type semiconductor.

If, on the other hand, $N_{a}$ is greater than $N_{d}$ and $N_{A} \gg n_{i}$, then

$$
\begin{gather*}
p_{o} \approx N_{A}  \tag{2.27}\\
n_{o}=\frac{n_{i}^{2}}{p_{o}} \approx \frac{n_{i}^{2}}{N_{A}} \tag{2.28}
\end{gather*}
$$

In this case the hole population is greatly increased over $n_{i}$, and the electron population is suppressed. The predominant mobile charge carriers are holes, and the semiconductor is said to be an extrinsic p-type. In a p-type semiconductor, holes are the majority carrier and electrons are the minority carrier.

## Example

Question. Consider a sample of silicon that contains $5 \times 10^{17} \mathrm{~cm}^{-3}$ boron atoms and $8 \times 10^{16} \mathrm{~cm}^{-3}$ arsenic atoms. What are the equilibrium hole and electron concentrations in this sample at room temperature?

Discussion. Boron is in column III of the periodic table and is thus an acceptor, and arsenic is in column V and is a donor. Thus $N_{a}$ is $5 \times 10^{17} \mathrm{~cm}^{-3}$ and $N_{d}$ is $8 \times 10^{16} \mathrm{~cm}^{-3}$; since $N_{a}$ is greater than $N_{d}$, we see that we have a net acceptor
concentration $N_{A}$, of $4.2 \times 10^{17} \mathrm{~cm}^{-3}$. Thus the sample is $p$-type, holes are the majority carrier, and the equilibrium hole concentration $p_{0}$ is approximately $N_{A}$. That is,

$$
p_{o}=4.2 \times 10^{17} \mathrm{~cm}^{-3}
$$

The equilibrium minority carrier (i.e., electron) concentration $n_{0}$, is given by Eq. (2.28). In silicon at room temperature, the intrinsic carrier concentration $n_{i}$ is $10^{10} \mathrm{~cm}^{-3}$, and $n_{i}^{2}$ is roughly $10^{20} \mathrm{~cm}^{-3}$. We thus find that

$$
n_{0}=2.4 \times 10^{2} \mathrm{~cm}^{-3}
$$

Notice that $p_{o}$ is much greater than $n_{i}$ in this extrinsic, $p$-type sample, whereas $n_{0}$ is much, much less than $n_{i}$.

### 2.4 ADDITIONAL SEMICONDUCTORS

Although silicon is by far the most widely used semiconductor, there are many other materials, both elements and compounds, that are semiconductors. Many are widely used in applications where silicon is not suitable, and we will have the opportunity to mention some of these applications as we study various devices.

### 2.4.1 Elemental Semiconductors

The column IV elements, carbon, silicon, germanium and tin, can all form diamond structure crystals, and all except tin are semiconductors. After Si, germanium is the most important. The energy gap of Ge is 0.7 eV . Much of the early research and development of semiconductor devices was done using Ge because it was initially easier to grow single crystals of Ge than of Si. Eventually, however, the lower sensitivity to temperature of Si and, more importantly, its advantageous processing features made it the material of choice.

Today germanium is used primarily in infrared optical detectors and in power diodes and transistors. Ge is used for infrared detectors because it has a much smaller bandgap than silicon, which makes it sensitive to lower-energy, longerwavelength light. In power device applications, Ge's smaller bandgap is also useful because it leads to a lower $p$ - $n$ diode forward turn-on voltage than the usual 0.6 or 0.7 V seen in Si diodes. The charge carriers in Ge are also more mobile than in Si , which is also an advantage; especially in high power devices. You will be in a much better position to appreciate these facts after we discuss diodes and transistors in later chapters.

### 2.4.2 Compound Semiconductors

Many compounds are semiconductors, but the most important are those formed of elements from columns III and V of the periodic table and, to a lesser extent, from columns II and VI. We speak of these as III-V ("three-five") and II-VI ("two-six") semiconductors, respectively. We will concentrate here on the III-V's, but much
of what we will say extends in very obvious ways to the II-VI's; key properties of many members of both families of materials are listed in Table A. 2 of App. A.

The III-V's are of practical interest in part because the conduction electrons are in general more mobile in them than in silicon, so the III-V's offer the possibility of producing faster devices. Furthermore, they tend to be more useful than silicon for many optical device applications. When holes and electrons recombine in many III-V compounds, the energy that is released is given up primarily as light, rather than thermal energy as with silicon. This makes these III-V's useful for making light-emitting diodes and laser diodes. It then becomes desirable to make other devices (i.e., transistors, detectors, modulators, etc.) from these same materials so that all the devices in an integrated system can be made of a common material or family of materials.

The III-V's and most of the II-VI's crystallize into a zinc-blend structure, named after the II-VI compound zinc sulfide, ZnS . We have already seen this structure in Fig. 2.3b. In a zinc-blend lattice, each of the face-centered cubic sublattices in the diamond structure is composed of a different element. For example, in the III-V compound gallium arsenide, GaAs, one of the sublattices is made of gallium atoms and the other is made of arsenic atoms.

Any of the elements in the middle part of column III of the periodic table [i.e., aluminum (Al), gallium (Ga), and indium (In)] can be combined with an element from column V [i.e., phosphorus ( P ), arsenic ( As ), and antimony ( Sb )] to form a useful III-V compound semiconductor. Since they involve two elements, these III-V's are also called binary compounds, or simply binaries. Of the nine possible binaries that can be formed from the elements just listed, the most important is gallium arsenide. It is widely used in high-frequency transistors for high-speed logic and communications, and in infrared laser diodes for compact disc players and fiber optics systems.

The spectrum of possible III-V compounds is greatly enlarged by the fact that binary compounds can be mixed to form ternary and quaternary compounds with properties intermediary between those of the constituent binaries. A common example is the ternary aluminum gallium arsenide, (AlAs) $x_{x}(\mathrm{GaAs})_{1-x}$, or, as it is more usually written, $\mathrm{Al}_{x} \mathrm{Ga}_{1-x} \mathrm{As}$, where $x$ is between 0 and 1 . The energy gap of $\mathrm{Al}_{x} \mathrm{Ga}_{1-x} \mathrm{As}$ falls between that of GaAs and AlAs, and, in a fortuitous twist of fate, all of these compounds have the same crystal size, that is, the same lattice constant. This makes it possible to fabricate $\mathrm{Al}_{x} \mathrm{Ga}_{1-x} \mathrm{As}$ layered structures on GaAs without worrying whether the crystals fit well together. The resulting structures, termed heterostructures, can be used to great adyantage in designing advanced device structures with significantly higher performance than achievable with a single semiconductor.

Other ternary compounds, however, do not in general have a lattice constant that is invariant with composition, and in order to produce lattice-matched heterostructures a fourth element must be added, yielding a quaternary. One example is indium gallium arsenide phosphide, $\mathrm{In}_{x} \mathrm{Ga}_{1-x} \mathrm{As}_{y} \mathrm{P}_{1-y}$, which can be used to produce heterostructures on indium phosphide, InP. This material system is of interest because it has band-gaps with lower energies than those of $\mathrm{Al}_{x} \mathrm{Ga}_{1-x} \mathrm{As}$.

It can thus be used in laser diodes emitting at longer wavelengths, where glass fibers are the most transparent and have their minimum dispersion. Materials in this quaternary system also have highly mobile conduction electrons and have been used to produce devices that operate even faster than do gallium arsenide-based devices.

We will only occasionally mention III-V compounds from now on in this text, and we will not deal at all with heterostructure devices-not because these topics are so complicated, but simply because there is only so much that a first electronic devices and circuits text should attempt to cover. Once you master the material and concepts presented here, their extension to new materials, and even to heterostructures, will be easy.

### 2.5 THE EFFECTS OF CHANGING TEMPERATURE

The semiconductors used in most modern electronic devices and integrated circuits (primarily silicon, but also germanium, gallium arsenide, and others) have been chosen and engineered for use at room temperature. This means, as we have discussed with respect to extrinsic silicon, that they have energy gaps that are large enough for the intrinsic carrier concentration at room temperatare to be sufficiently small that, without dopants, the semiconductor is effectively an insulator. It also means that the ionization energies of the chosen dopants are small enough that the dopants are totally ionized at room temperature. Thus, for example, boron is used in silicon when an acceptor is desired, whereas indium, another column III element, is not. The ionization energy of indium in Si is too large, and only a small fraction of the indium atoms in a Si crystal are ionized at room temperature. The semiconductors we use in room-temperature applications tend to have energy gaps greater than roughly 0.5 eV . If the energy gap is much smaller, the intrinsic carrier concentration will be too high and will dominate over any impurities we might introduce, making it impossible to make the material either strongly $n$ - or $p$-type rather than simply intrinsic.

Now that we understand that semiconductors must be chosen and engineered (i.e., designed) for use in specific temperature ranges, we need to understand what happens to these materials as we change the temperature significantly from the "design" value. We will continue to focus on room temperature in most of our discussions without quantifying the effects of temperature change, but we do want to have at least a qualitative understanding of what happens. We will consider an extrinsic silicon sample and look first at decreasing, and then increasing, its temperature.

As the temperature is decreased, our assumption that all of the donors and acceptors are ionized eventually becomes invalid, and Eqs. (2.2) and (2.5) can no longer be used. They must be replaced by more accurate relationships derived from statistical mechanics (see App. C, Sec. C.1). But this is the only change that must be made. It remains true that the product $n_{o} \cdot p_{o}$ is $n_{i}^{2}$. (Note, however, that $n_{i}$ is much lower at lower $T$, as the next paragraph shows.) Furthermore, our
expressions for the equilibrium carrier concentrations, Eqs. (2.25) and (2.26) for $n$-type material and Eqs. (2.27) and (2.28) for $p$-type, remain valid if the net donor and acceptor concentrations, respectively, are replaced by the net ionized donor and net ionized acceptor concentrations, and if the proper value of the intrinsic carrier concentration is used. Reexamination of these equations will show you that if the donors and acceptors are not fully ionized, the equilibrium carrier concentrations will be lower than if the dopants were fully ionized. This loss of mobile carriers to un-ionized dopant atoms as temperature is lowered is termed freeze-out.

As the temperature is increased above the extrinsic temperature region (room temperature in the present example), we must be concerned about the intrinsic carrier concentration $n_{i}$. This concentration is a very sensitive function of temperature, which statistical mechanics teaches us can be written approximately as

$$
\begin{equation*}
n_{i}(T)=A T^{3 / 2} \exp \left(\frac{-E_{g}}{2 k T}\right) \tag{2.29a}
\end{equation*}
$$

where $A$ is some constant and $E_{g}$ is the energy gap. It is sometimes convenient to write this in terms of $n_{i}$ at room temperature ( 300 K ):

$$
\begin{equation*}
n_{i}(T)=n_{i}(300 \mathrm{~K})\left(\frac{T}{300}\right)^{3 / 2} \exp \left\{-\left[E_{g}\left(\frac{1}{2 k T}-\frac{1}{600 k}\right)\right]\right\} \tag{2.29b}
\end{equation*}
$$

In either form, we see that as temperature increases, the intrinsic carrier concentration increases exponentially and will eventually exceed the net doping concentration (donor or acceptor) and the sample will no longer appear extrinsic. Both the equilibrium hole and electron concentrations again approach $n_{i}$, and the material becomes intrinsic, and, as we shall see, useless for devices. In silicon this situation does not occur until very high temperatures, but in germanium, for example, which has a much smaller energy gap $\Delta E_{g}$, this may occur at several hundred degrees centigrade.

The variation of the equilibrium majority carrier concentration as function of temperature in a generic semiconductor can be summarized by the graph in Fig. 2.9. The asymptotic dependences of the concentration on temperature in each of the three regions, freeze-out, extrinsic, and intrinsic, are indicated. Our objective in designing devices is to choose materials that operate in their extrinsic regime for the intended device applications.

### 2.6 SUMMARY

We have seen in this chapter that there are two types of mobile charge carriers in semiconductors, holes and electrons, and that we can engineer the dominant carrier type and its concentration by adding specific impurities, called dopants, to semiconductor crystals. An important conclusion we reached was that the product of the hole and electron concentrations, $p_{0}$ and $n_{o}$, respectively, in thermal equilibrium is $n_{i}^{2}$, where $n_{i}$ is the intrinsic carrier concentration. That is,

$$
n_{o} \cdot p_{o}=n_{i}^{2}(T)
$$



FIGURE 2.9
Variation of the equilibrium electron concentration over a wide temperature range for a representative $n$-doped semiconductor sample. The vertical axis is a logarithmic scale; the horizontal axis is inverse temperature, $1 / T$. With this choice of axes the asymptotic behavior of the carrier concentration is linear in each of the three regions: freeze-out, extrinsic, and intrinsic.

This result, combined with the requirement of charge conservation,

$$
n_{o}+N_{a}^{--}=p_{o}+N_{d}^{+}
$$

allows us to determine $n_{0}$ and $p_{0}$ given the donor and acceptor concentrations. Assuming full ionization, we have

$$
\begin{array}{lll}
n \text {-type }: & n_{0} \approx N_{D}, & p_{0}=\frac{n_{i}^{2}}{n_{0}},
\end{array} \quad \text { with } N_{D} \equiv N_{d}-N_{a} .
$$

Our focus has been on silicon at room temperature, but we have also seen that there are numerous other semiconductors, many of which are of great practical interest and importance. Some of these are single elements from column IV of the periodic table (e.g., Ge) but the largest number are based on binary compounds formed of elements from columns III and V or from columns II and VI. Binary compounds can be used alone (e.g., GaAs and CdTe ) or alloyed with
other binaries to form ternary and quaternary semiconductors (e.g., $\mathrm{Al}_{x} \mathrm{Ga}_{1-x} \mathrm{As}$ and $\mathrm{In}_{x} \mathrm{Ga}_{1-x} \mathrm{As}_{y} \mathrm{P}_{1-y}$ ).

Finally, we have seen the features of silicon and its dopants that make it attractive for use around room temperature, and we have discussed qualitatively what to expect as the temperature is increased above or decreased below room temperature.

## PROBLEMS

2.1 A sample of silicon is uniformly doped with $10^{16}$ arsenic atoms per $\mathrm{cm}^{3}$ and $5 \times 10^{15}$ boron atoms per $\mathrm{cm}^{3}$. Using this information and assuming $n_{i}$ is $10^{10} \mathrm{~cm}^{-3}$ at 300 K determine the following items for this sample at $T \approx 300 \mathrm{~K}$ :
(a) The type ( $n$ or $p$ )
(b) The majority carrier concentration
(c) The minority carrier concentration.

Repeat parts (a) and (b) when
(d) The sample instead contains $10^{17} \mathrm{~cm}^{-3} \mathrm{Al}$ and $10^{16} \mathrm{~cm}^{-3} \mathrm{Sb}$
(e) The sample instead contains $10^{15} \mathrm{~cm}^{-3} \mathrm{Ga}$ and $5 \times 10^{15} \mathrm{~cm}^{-3} \mathrm{~B}$
2.2 (a) A germanium ( $n_{i}=2.4 \times 10^{13} \mathrm{~cm}^{-3}$ at 300 K ) sample is doped with $6 \times 10^{16} \mathrm{~cm}^{-3}$ arsenic atoms (donors).
(i) What are $n_{o}$ and $p_{0}$ at 300 K in this sample?
(ii) An additional $10^{18} \mathrm{~cm}^{-3}$ gallium atoms (acceptors) are added to this specimen. What are the new $n_{o}$ and $p_{o}$ ? (Note: Assume full ionization.)
(b) Determine the carrier type of a sample of the covalent semiconductor indium phosphide, InP, containing the following substitutional impurities:
(i) Te substituting for $P$
(ii) Be substituting for In
(iii) Si substituting for P
(iv) Si substituting for In
2.3 (a) An intrinsic semiconductor has the following characteristics: intrinsic carrier concentration $n_{i}$, electron mobility $\mu_{e}$, and hole mobility $\mu_{h}$; where $\mu_{e}>\mu_{h}$. When this semiconductor is doped with a certain impurity, it is found that its conductivity initially decreases as the doping concentration is increased. It eventually increases, however, as still more dopant is added.
(i) What type of impurity is being added: donor or acceptor?
(ii) Find an expression for the initial rate of change of conductivity with dopant concentration (i.e., find the initial value of $d \sigma / d N$ ). You will find that the answer depends in a simple way on the difference between the two mobilities.
(b) The intrinsic carrier concentration $n_{i}$ varies with temperature as

$$
T^{3 / 2} \exp \left(-E_{g} / 2 k T\right)
$$

where $k=8.62 \times 10^{-5} \mathrm{eV} / \mathrm{K}$.
(i) Calculate $n_{i}$ for Ge at the following temperatures given that $n_{i}=2.4 \times$ $10^{13} \mathrm{~cm}^{-3}$ at 300 K . Neglect any change of $E_{g}$ with $T$, and assume $E_{g} \doteq$ 0.67 eV .
(l) $-23^{\circ} \mathrm{C}(250 \mathrm{~K})$
(2) $127^{\circ} \mathrm{C}(400 \mathrm{~K})$
(3) $327^{\circ} \mathrm{C}(600 \mathrm{~K})$
(ii) At which of the temperatures in part (i) would a Ge sample with $N_{D}=$ $1 \times 10^{16} \mathrm{~cm}^{-3}$ be considered "extrinsic"?
(iii) Which of the factors in the expression for $n_{i}$ dominates its temperature dependence?
2.4 How large must $|N| / n_{i}$ be in order for the minority carrier concentration to be less than 10 percent of the majority density? Less than 1 percent?
2.5 Consider an $n$-type silicon sample at room temperature. It is known that $n_{0}$ in this sample is $5 \times 10^{16} \mathrm{~cm}^{-3}$. It is also known that this sample contains arsenic in a concentration of $6 \times 10^{16} \mathrm{~cm}^{-3}$.
(a) This sample is known to also contain one other impurity, either phosphorus or boron.
(i) Which impurity is it and why?
(ii) What is the concentration of this impurity?
(b) What is the room-temperature thermal-equilibrium hole concentration in this sample? Assume $n_{i}=1.0 \times 10^{10} \mathrm{~cm}^{-3}$.
2.6 One important model for a substitutional donor atom ( $\mathrm{P}, \mathrm{As}$, or Sb ) in silicon is the hydrogenic donor model. In this model it is assumed that the "extra" fifth electron and the positively charged donor ion can be modeled much like the electron and positively charged ion (proton) of a hydrogen atom. The only necessary modifications are that the dielectric constant must be changed from that of free space to that of the semiconductor, and the mass of the electron must be changed from that of a free electron to that of an electron in the semiconductor.

The binding energy and orbital radius of the electron in a hydrogen atom are given by

$$
\begin{aligned}
E_{0} & =\frac{q^{4} m_{0}}{8 h^{2} \varepsilon_{0}^{2}}=13.6 \mathrm{eV} \\
r_{o} & =\frac{h^{2} \varepsilon_{0}}{\pi q m_{0}}=0.53 \AA
\end{aligned}
$$

(a) Use this information to calculate the binding energy and the orbital radius of the electron associated with a hydrogenic donor (i.e., a donor that can be described by the hydrogenic model). In silicon, $m_{e} / m_{0}=0.26$ and $\varepsilon / \varepsilon_{0}=11.7$.
(b) How does the orbital radius compare with the space between Si atoms in the lattice, which is approximately $2.5 \AA$ ? How many silicon atoms would be encompassed by the sphere defined by the orbital radius? The unit cube (cell) of the Si lattice is $5.43 \AA$ on a side, and there are eight atoms per unit cell.
(c) At what density of donor atoms would the orbital spheres of their electrons begin to overlap?
2.7 Silicon is an interesting dopant for gallium arsenide, an important compound semiconductor. If Si replaces Ga in, the crystal, it acts like a donor; if it replaces As it is an acceptor. Which site it occupies depends on how the dopant was introduced and the thermal history of the sample. Heat-treating the sample can also cause some of the Si to move from As to Ga sites, or vice versa, depending on the temperature.
(a) A certain sample of gallium arsenide, GaAs, is known to contain $5 \times 10^{17} \mathrm{~cm}^{-3} \mathrm{Si}$ atoms and to be n-type with a net donor concentration of $3 \times 10^{17} \mathrm{~cm}^{-3}$. What is the concentration of Si atoms on Ga sites (i.e., $N_{d}$ ), and what is the concentration on As sites (i.e., $N_{a}$ )?
(b) Suppose that after a particular heat cycle, the net donor concentration is reduced by a factor of two. What type of dopant redistribution has occurred, and what are the values of $N_{d}$ and $N_{a}$ now?
2.8 Four different compound semiconductors and their bandgap energies are listed below. For each semiconductor calculate the longest wavelength of light that will pass through it, without being absorbed, to create hole-electron pairs. Indicate also whether each will appear opaque, like silicon, or will transmit visible light; and if it does, what color will it appear? Note that wavelength in microns and energy in electron volts are related as $\lambda(\mu \mathrm{m})=1.237 / E_{g}(\mathrm{eV})$, and that visible light falls between $0.4 \mu \mathrm{~m}$ and $0.7 \mu \mathrm{~m}$.
(a) AlSb , aluminum antimonide: $\quad E_{g}=1.63 \mathrm{eV}$
(b) GaP, gallium phosphide: $\quad E_{g}=2.24 \mathrm{eV}$
(c) ZnS , zinc sulfide: $\quad E_{g}=3.6 \mathrm{eV}$
(d) InAs, indium arsenide: $\quad E_{g}=0.33 \mathrm{eV}$

## CHAPTER

 3
## UNIFORM EXCITATION OF SEMICONDUCTORS

Now that we have a model describing a uniformly doped semiconductor in thermal equilibrium, we are ready to disturb this thermal equilibrium and watch how the semiconductor responds. We hope that something will happen that we can exploit to perform some useful function. We will start modeling nonequilibrium conditions by restricting ourselves to uniformly doped semiconductors and by applying uniform excitations. We will look at two types of excitation: (1) a uniform electric field, and (2) uniform optical carrier generation.

### 3.1 UNIFORM ELECTRIC FIELD: DRIFT

One of the first devices about which an electrical engineer learns is a linear resistor, and one of the first laws he or she learns is Ohm's law. So, too, will the microscopic formulation of resistance and Ohm's law arise first as we begin our look at semiconductors in nonequilibrium situations. We first introduce the concept of drift motion and mobility and then turn to drift currents and conductivity.

### 3.1.1 Drift Motion and Mobility

A charged particle, which we will identify with the index $I$, in a uniform electric field $\mathscr{E}$ experiences a force $\mathbf{F}$ given by

$$
\begin{equation*}
\mathbf{F}=q_{I}^{\mathscr{E}} \tag{3.1}
\end{equation*}
$$

where $q_{I}$ is the electric charge on the particle. For sake of convenience and simplicity in this text we will assume that the field is directed in the $x$-direction
and that we are dealing with isotropic materials. Thus we do not need to use vector notation, and deal only with scalars. We will have

$$
\begin{equation*}
F_{x}=q_{I} \mathscr{E}_{x} \tag{3.2}
\end{equation*}
$$

If the charged particle in question is in free space, the force $F_{x}$ will cause the particle to accelerate as

$$
\begin{equation*}
a_{x}=\frac{F_{x}}{m_{I}}=\frac{q_{I} \mathscr{E}_{x}}{m_{I}} \tag{3.3}
\end{equation*}
$$

where $m_{I}$ is the mass of the particle. The particle will accelerate until it hits something, that is, has an interaction with its surroundings.

If the charged particle is inside a solid, as is the case with a conduction electron or a mobile hole in a semiconductor, it will typically hit something very quickly (e.g., a dopant ion in the lattice, the vibrating atoms in the crystal lattice, defects in the crystal structure, etc.) and it will do so after traveling only a relatively short distance. At this point it exchanges energy and momentum with whatever obstacle it encounters, rebounds or is deflected, and starts being accelerated again due to the force of the field. The net motion is quite different than the constant acceleration of a free charged particle and instead is very viscous. The particle attains a net average velocity proportional to the field given by

$$
\begin{equation*}
\bar{s}_{x}= \pm \mu_{I} \mathscr{E}_{x} \tag{3.4}
\end{equation*}
$$

where the proportionality factor $\mu_{I}$ is called the mobility of the particle $I$ and the $\operatorname{sign}\left(+\right.$ or - ) is the same as the sign of the charge of the particle, $q_{I}$. The mobility is in general a function of the electric field, but in many situations encountered in devices it can be assumed to be a constant independent of $\mathscr{E}_{x}$ (see below).

Notice that above we speak of an average net velocity. We do so because even in the absence of an electric field the particles are in constant motion with large, yet random, velocities due to their thermal energy. Recall that we earlier stated that at a finite temperature the atoms in a crystal are constantly vibrating due to their thermal energy. The conduction electrons and mobile holes also have thermal energy; they move about, deflecting off obstacles, exchanging energy and momentum, and literally bouncing back and forth. The average magnitude of the thermal velocity of electrons and holes in a semiconductor is in fact quite large at room temperature-on the order of $10^{6}$ to $10^{7} \mathrm{~cm} / \mathrm{s}$-yet the net average velocity is zero. Thus in the absence of an electric field there is no net motion of the holes or electrons. This situation is illustrated for a conduction electron in Fig. 3.1a.

When a uniform electric field is applied, the carriers are accelerated slightly by the field between collisions; averaged over many collisions they acquire a net average velocity. This is illustrated in Fig. 3.1b. The collisions occur at a high rate, on the order of $10^{12}$ a second, or once every picosecond. Unless we are studying things that happen this fast, we "see" only the net average velocity of the particles.


FIGURE 3.1
(a) Pictorial illustration of the continuous random thermal motion of a conduction electron in a semiconductor lattice. (b) The same electron with an electric field applied from right to left, exhibiting net motion superimposed on the random thermal motion.

The motion of charged particles in an electric field and with a net average velocity proportional to the field is called drift. In semiconductors, where the particles of interest are electrons and holes, we write for electrons

$$
\begin{equation*}
\bar{s}_{e x}=-\mu_{e} \mathscr{C}_{x} \tag{3.5}
\end{equation*}
$$

and for holes

$$
\begin{equation*}
\bar{s}_{h x}=\mu_{h} \mathscr{E}_{x} \tag{3.6}
\end{equation*}
$$

Notice that the net motion of the holes is in the direction of the field, whereas the electrons move in the opposite direction. These directions are, of course, the same as those in which positively and negatively charged particles accelerate in free space.

For low to moderate electric fields the mobility is constant and not a function of the electric field. Thus in low and moderate electric fields the drift velocity is linearly proportional to the electric field.

At very high electric fields, as the drift velocity begins to approach the thermal velocity (i.e., $10^{6}$ to $10^{7} \mathrm{~cm} / \mathrm{s}$ ) we find that the velocity saturates in the vicinity of $10^{6} \mathrm{~cm} / \mathrm{s}$. The carriers suffer collisions so rapidly and transfer energy to the lattice so quickly that increasing the electric field no longer increases the kinetic energy of the carriers.

To illustrate this the overall variation of the drift velocity with electric field strength in silicon is presented in Fig. 3.2. Most carrier drift motion in devices occurs in the linear part of this curve, but increasingly there are key regions in modern devices in which carriers are moving at their saturation velocity. Examples of this are especially prevalent in field effect devices.


FIGURE 3.2
Log-log plot of the net drift velocity of electrons and holes as a function of the electric field in high-purity silicon at 300 K. (Reproduced from Yang, E., Microelectronic Devices, 1988, with permission from. McGraw-Hill, Inc.)

It is possible to model the motion and collisions of charge carriers in a solid in more detail than we have shown here. It is from such models that the numbers stated earlier for the rate of collisions and the distances traveled between collisions were obtained, but we will not go further in this text. This means, however, that we should not expect our model of viscous flow and drift to be able to successfully model events happening on a time scale comparable to or less than the mean time between collisions, or on a distance scale comparable to or less than the mean collision length. This is not a severe restriction for most present-day devices, but we should know that it exists and that it places bounds on our modeling. It begins to become important in extremely small devices wherein carriers can transit all or most of the device before suffering a collision. In this case their motion is described by Eq. (3.3) and their motion is said to be ballistic.

### 3.1.2 Drift Current and Conductivity

Moving charged particles make up an electric current. This is the macroscopic consequence of applying an electric field to a solid. To explore this further, consider a semiconductor sample with thermal-equilibrium hole and electron concentrations $p_{0}$ and $n_{0}$, respectively, and imagine applying a uniform electric field $\mathscr{E}_{x}$ in the $x$-direction. If the field is not too large, the electron and hole populations remain at $p_{o}$ and $n_{o}$, respectively. The net flux density of electrons crossing any plane normal to the $x$-direction, $F_{e x}$, will in general be

$$
\begin{equation*}
F_{e x}=n_{o} \bar{s}_{e x} \tag{3.7a}
\end{equation*}
$$

and, at low to moderate electric fields where Eq. (3.5) holds,

$$
\begin{equation*}
F_{e x}=-n_{o} \mu_{e} \mathscr{E}_{x} \tag{3.7b}
\end{equation*}
$$

Since each electron carries a charge $-q$, the net electron current density $J_{e x}$, due to the electric field will be

$$
\begin{equation*}
J_{e x}=q n_{o} \mu_{e} \mathscr{g}_{x} \tag{3.8}
\end{equation*}
$$

Similarly for holes, the hole flux density $F_{h x}$ will be

$$
\begin{equation*}
F_{h x}=p_{o} \mu_{h} \mathscr{E}_{x} \tag{3.9}
\end{equation*}
$$

and the hole current density due to the electric field will be

$$
\begin{equation*}
J_{h x}=q p_{o} \mu_{h} \mathscr{E}_{x} \tag{3.10}
\end{equation*}
$$

The total current density $J_{x}$ is the sum of the hole and electron current densities;

$$
\begin{equation*}
J_{x}=J_{e x}+J_{h x} \tag{3.11}
\end{equation*}
$$

or, substituting from Eqs (3.8) and (3.10),

$$
\begin{equation*}
J_{x}=q\left(n_{o} \mu_{e}+p_{o} \mu_{h}\right)_{\mathscr{E}_{x}} \tag{3.12}
\end{equation*}
$$

This current is called the drift current density. The quantity $q\left(n_{o} \mu_{e}+p_{o} \mu_{h}\right)$ is called the conductivity and is given the symbol $\sigma$. The units of conductivity are siemens per centimeter, $\mathrm{S} / \mathrm{cm}$. Thus we can write

$$
\begin{equation*}
J_{x}=\sigma_{\mathscr{C}_{x}} \tag{3.13}
\end{equation*}
$$

The inverse of the conductivity is called the resistivity $\rho$ :

$$
\begin{equation*}
\rho=\frac{1}{\sigma} \tag{3.14}
\end{equation*}
$$

The units of resistivity are ohm-centimeters, $\Omega \cdot \mathrm{cm}$.
Equation (3.13) is the microscopic statement of Ohm's law, $v=i R$. The resistance $R$ of a sample depends on its dimensions and its conductivity. Suppose a sample of length $l$, width $w$, and thickness $t$ has electrical contacts $A$ and $B$ on either end with a voltage difference $v_{A B}$ between them. We will discuss contacts at length later, but for now assume they are "ideal ohmic" contacts and that all of the voltage difference is across the sample, so that it has in it a uniform electric field

$$
\begin{equation*}
\mathscr{E}_{x}=\frac{v_{\mathrm{AB}}}{l} \tag{3.15}
\end{equation*}
$$

The current density at any point in the bar will then be

$$
\begin{equation*}
J_{x}=\frac{\sigma v_{\mathrm{AB}}}{l} \tag{3.16}
\end{equation*}
$$

and the total current will be the current density multiplied by the cross-sectional area of the sample, wt. That is,

$$
\begin{equation*}
i=J_{x} w t=\frac{\sigma w t}{l} v_{\mathrm{AB}} \tag{3.17}
\end{equation*}
$$

We can now easily identify the resistance of the sample as

$$
\begin{equation*}
R=\frac{l}{\sigma w t}=\rho \frac{l}{w t} \tag{3.18}
\end{equation*}
$$

In semiconductors the equilibrium carrier concentrations can be varied over many orders of magnitude, as we saw in Chap. 2. Moreover, it is possible to dope a sample so that either holes or electrons are in the majority by a vast amount. Looking back at our expression that introduced conductivity, Eq. (3.12), we see that the conductivity can similarly vary over wide ranges, and that the drift current can be carried predominantly by either holes or electrons. In an $n$-type semiconductor, the drift current due to electrons is far greater than that due to holes (assuming that the electron and hole mobilities are of the same order of magnitude, which they typically are). Similarly, in a $p$-type semiconductor the drift current is predominantly carried by holes.

The electron and hole mobilities in a semiconductor in general depend on the concentrations of dopants present as well as on the temperature and the number of structural defects in the crystal. Generally, the higher the doping level, the higher the temperature; and the larger the number of defects, the lower the mobility. In this text, we will assume that mobilities of the carriers in a given sample have been measured experimentally; a method for doing this for the majority carriers, the Hall effect measurement technique, is described in App. B. Representative values of the electron and hole mobilities in high-quality silicon at room temperature are $1500 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}$ for $\mu_{e}$, and $600 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}$ for $\mu_{h}$.

## Example

Question. What is the conductivity at room temperature of (a) intrinsic silicon, (b) Si doped $n$-type with $N_{D}=10^{16} \mathrm{~cm}^{-3}$, and (c) Si doped $p$-type with $N_{A}=$ $10^{16} \mathrm{~cm}^{-3}$ ? Use $n_{i}=10^{10} \mathrm{~cm}^{-3}$; use the carrier mobilities stated just above.

## Discussion.

(a) In intrinsic Si, $n_{0}$ and $p_{o}$ are equal to $n_{i}$ and we find that the conductivity is $3.5 \times 10^{-6} \mathrm{~S} / \mathrm{cm}$. To put this in perspective, the conductivity of a typical metal is on the order of $10^{6} \mathrm{~S} / \mathrm{cm}$ and that of a good insulator is $10^{-12} \mathrm{~S} / \mathrm{cm}$. Intrinsic Si is thus closer to being an insulator than a metal.
(b) For Si doped $n$-type with $N_{D}=10^{16} \mathrm{~cm}^{-3}$, our calculations give $n_{o}=$ $10^{16} \mathrm{~cm}^{-3}$ and $p_{o}=10^{4} \mathrm{~cm}^{-3}$. Thus the conductivity $\sigma$ is $2.4 \mathrm{~S} / \mathrm{cm}$ and, equivalently, the resistivity $\rho$ is approximately $0.4 \Omega \cdot \mathrm{~cm}$. This conductivity is essentially all due to electrons (i.e., the majority carriers).
(c) A $p$-type sample doped with the same magnitude of net acceptors (i.e., $N_{A}=$ $10^{16} \mathrm{~cm}^{-3}$ ) has a lower conductivity than the $n$-type sample because the hole mobility is less than that of electrons. With $N_{A}=10^{16} \mathrm{~cm}^{-3}$, we find that $p_{0}=10^{16} \mathrm{~cm}^{-3} ; n_{0}=10^{4} \mathrm{~cm}^{-3} ;$ and $\sigma \approx 1 \mathrm{~S} / \mathrm{cm}$, or $\rho \approx 1 \Omega \cdot \mathrm{~cm}$.

In both of the doped semiconductors considered in the example above, the conductivity is much less than that of a good metal, but it is high enough to be useful. In most semiconductor devices the doping levels range from $10^{15} \mathrm{~cm}^{-3}$ to $10^{18} \mathrm{~cm}^{-3}$. Correspondingly, the conductivity ranges from $0.1 \mathrm{~S} / \mathrm{cm}$ to over $200 \mathrm{~S} / \mathrm{cm}$.

### 3.1.3 Temperature Variation of Mobility and Conductivity

Before leaving uniform electrical excitation and the concept of drift, we would do well to ask how temperature affects mobility and conductivity. By developing detailed models for carrier motion in a solid and for the various collision, or "scattering," processes that the carriers experience, it is possible to show that in general the mobility decreases as the temperature increases. This result, which we will not attempt to quantify in this text, should seem feasible to you; at higher temperatures there is more random motion of the crystal lattice, so it is reasonable that the carriers suffer more collisions and that their motion is impeded. In silicon the mobility decreases as $T^{-1 / 2}$ above room temperature, whereas for most compound semiconductors the mobility falls as $e^{-\theta / T}$, where $\theta$ is a characteristic phonon temperature. As the temperature is lowered below room temperature, the mobility increases, at least initially. As the temperature becomes very low, however, collisions with impurities and defects in the crystal lattice become more important than the thermal motion of the lattice (i.e., the phonons). Thus the mobility eventually saturates and does not increase more. At even lower temperatures it may even decrease as the temperature is lowered further because the defects and impurities are actually more effective scattering centers at low temperature.

The conductivity involves both the mobility and the carrier concentration and thus can have a more complicated dependence on temperature. We discussed the temperature dependence of the carrier concentration in Sec. 2.5. In extrinsic semiconductors around room temperature, the carrier concentration is largely temperature-independent, so the conductivity will decrease along with the mobility as the temperature is increased. At high enough temperature, when the sample becomes intrinsic, the carrier concentration increases very rapidly with temperature and the conductivity also increases. At low temperature, where freeze-out occurs, the conductivity may either increase or decrease depending on whether freeze-out or the increase in mobility dominates. Typically the conductivity will at first increase as the temperature is lowered below room temperature because the mobility increases, but ultimately the conductivity will decrease with temperature at very low temperatures, say below 70 to 80 K , because of the freeze-out and the eventual decrease of mobility.

### 3.2 UNIFORM OPTICAL EXCITATION

A second important way that semiconductors can be forced out of thermal equilibrium is by illuminating them with light of energy greater than the energy gap.

In Si , where $E_{g}=1.1 \mathrm{eV}$, this corresponds to light in the visible and ultraviolet regions of the spectrum as well as very near-infrared radiation. In this section we will consider optical excitation of semiconductors with such light.

### 3.2.1 Minority Carrier Lifetime

We discussed hole-electron pair generation and recombination mechanisms in Chap. 2 when we discussed detailed balance. We defined the generation rate as $G$ and the recombination rate as $R$. Clearly the time rate of change of the hole and electron populations in a uniform sample with uniform excitation will be the excess of generation over recombination:

$$
\frac{d n}{d t}=\frac{d p}{d t}=G-R
$$

If we write $R$ as $n p r$, this becomes

$$
\begin{equation*}
\frac{d n}{d t}=\frac{d p}{d t}=G-n p r \tag{3.19}
\end{equation*}
$$

In thermal equilibrium, $n=n_{o}, p=p_{o}$, and $d n / d t=d p / d t=0$. Thus we must have

$$
\begin{equation*}
G_{o}=n_{o} p_{o} r \tag{3.20}
\end{equation*}
$$

Now we will consider adding an external generation term in the form of light, which generates hole electron pairs uniformly throughout the sample at a rate $g_{L}(t)$. The total generation rate becomes

$$
\begin{equation*}
G=G_{o}+g_{L}(t) \tag{3.21}
\end{equation*}
$$

and we want to calculate the new carrier concentrations. We have

$$
\begin{equation*}
\frac{d n}{d t}=\frac{d p}{d t}=G_{0}+g_{L}(t)-n p r \tag{3.22}
\end{equation*}
$$

Substituting Eq. (3.20) in this equation yields

$$
\begin{equation*}
\frac{d n}{d t}=\frac{d p}{d t}=g_{L}(t)-\left(n p-n_{o} p_{o}\right) r \tag{3.23}
\end{equation*}
$$

This is a nonlinear differential equation because of the product term, $n p$. It is, in general, difficult to solve. To proceed further, we can get solutions in some important special cases if we first define the excess populations of holes and electrons, $p^{\prime}$ and $n^{\prime}$, respectively, as follows:

$$
\begin{align*}
& n^{\prime} \equiv n-n_{0}  \tag{3.24a}\\
& p^{\prime} \equiv p-p_{0} \tag{3.24b}
\end{align*}
$$

Using these definitions we can write $n$ and $p$ as

$$
\begin{align*}
& n=n_{0}+n^{\prime}  \tag{3.25a}\\
& p=p_{o}+p^{\prime} \tag{3.25b}
\end{align*}
$$

Next, notice that any carriers created in excess of the thermal equilibrium populations are always created in pairs; that is, for every excess hole there is an excess electron. Thus we must have

$$
\begin{equation*}
n^{\prime}=p^{\prime} \tag{3.26}
\end{equation*}
$$

The thermal equilibrium populations do not change with time, so we can also write

$$
\begin{equation*}
\frac{d n}{d t}=\frac{d n^{\prime}}{d t} \quad \text { and } \quad \frac{d p}{d t}=\frac{d p^{\prime}}{d t} \tag{3.27}
\end{equation*}
$$

Using the definitions of $n^{\prime}$ and $p^{\prime}$ and the observations we just made, we can now write Eq. (3.23) as

$$
\frac{d n^{\prime}}{d t}=g_{L}(t)-\left[\left(n_{0}+n^{\prime}\right)\left(p_{o}+n^{\prime}\right)-n_{o} p_{o}\right] r
$$

or

$$
\begin{equation*}
\frac{d n^{\prime}}{d t}=g_{L}(t)-n^{\prime}\left(p_{o}+n_{o}+n^{\prime}\right) r \tag{3.28}
\end{equation*}
$$

This now is one equation in one unknown, $n^{\prime}$, but it is still nonlinear because of the $\left(n^{\prime}\right)^{2}$ term, and it is in general difficult to solve. If the squared term is relatively small, however, we might be able to neglect it, in which case we have a simple first-order linear differential equation.

The situation where $n^{\prime}$ is small is called the low-level injection condition. By small we mean that $n^{\prime}$ (which equals $p^{\prime}$ ) is much smaller than the majority carrier population; that is,

$$
\begin{equation*}
n^{\prime}=p^{\prime} \ll \dot{p}_{o}+n_{0} \tag{3.29}
\end{equation*}
$$

In this case we have

$$
\begin{equation*}
n^{\prime}\left(p_{o}+n_{o}+n^{\prime}\right) \approx n^{\prime}\left(p_{0}+n_{o}\right) \tag{3.30}
\end{equation*}
$$

and our equation is

$$
\begin{equation*}
\frac{d n^{\prime}}{d t} \approx g_{L}(t)-n^{\prime}\left(p_{o}+n_{o}\right) r \tag{3.31}
\end{equation*}
$$

Defining $\left(p_{0}+n_{o}\right) r$ to be $\left(\tau_{\min }\right)^{-1}$, we write

$$
\begin{equation*}
\frac{d n^{\prime}}{d t}+\frac{n^{\prime}}{\tau_{\min }}=g_{L}(t) \tag{3.32}
\end{equation*}
$$

which is an equation that we can solve given $g_{L}(t)$ and information on the initial state of the sample.

We should point out that although $\tau_{\min }$ is written as $1 /\left(p_{o}+n_{o}\right) r$, it is wrong to assume that $\tau_{\min }$ varies inversely with the total carrier concentration because $r$ may, and in general does, depend on the carrier concentrations as well. It is
better to think simply in terms of a certain $\tau_{\min }$ for a given sample. This $\tau_{\min }$ is the consequence of the sample's purity, quality, composition, etc.-anything that might contribute a term to Eq. (2.14). However, developing a specific model relating $\tau_{\min }$ to $p_{o}, n_{o}$, and/or $r$ is beyond the scope of this text. In practice $\tau_{\min }$ is usually determined experimentally, rather than theoretically, by measuring population transients such as those discussed below in Sec. 3.2.2.

Before discussing solutions to Eq. (3.32), we make a final note that we could solve for either $n^{\prime}$ or $p^{\prime}$ but that we choose to solve for the excess minority carrier concentration. When we discuss nonuniform excitations, we will see that the minority carriers are the most important to us; we focus on minority carriers here in anticipation of that result. Furthermore, the quantity $\tau_{\min }$ is called the minority carrier lifetime, again in anticipation of this result.

### 3.2.2 Population Transients

For the sake of this discussion, let's assume that we are dealing with a uniformly doped, $p$-type sample of silicon. The equilibrium hole population $p_{o}$ is then $N_{A}$, and the equilibrium electron population is $n_{i}^{2} / N_{A}$. Suppose that $g_{L}(t)$ hole-electron pairs are being generated optically throughout the sample and we want to know what the excess hole and electron populations are. The equations we must solve are

$$
\begin{equation*}
\frac{d n^{\prime}}{d t}+\frac{n^{\prime}}{\tau_{e}}=g_{L}(t) \tag{3.33}
\end{equation*}
$$

where $\tau_{e}$ is $\tau_{\text {min }}$ in this $p$-type sample, and

$$
\begin{equation*}
p^{\prime}=n^{\prime} \tag{3.34}
\end{equation*}
$$

Equation (3.33) is a first-order linear differential equation. To solve it we need to find its homogeneous solution and a particular solution, which depends on $g_{L}(t)$. We then need to determine the relevant initial (boundary) condition and combine the homogeneous and particular solutions so as to satisfy it. The result is the total solution.

The homogeneous solution to Eq. (3.33) is

$$
\begin{equation*}
n^{\prime}=A e^{-t / \tau_{e}} \tag{3.35}
\end{equation*}
$$

where $A$ is a constant that will ultimately be determined by fitting the sum of the homogeneous and particular solutions to the boundary condition. We see that the minority carrier lifetime $\tau_{e}$ is the characteristic response time of the homogeneous solution.

The particular solution depends on the particular $g_{L}(t)$ imposed.

## Example

Question. What are the excess electron populations with the following types of lowlevel optical excitation: a) constant illumination; b) step-on, step-off illumination, c) square wave illumination; and d) steady sinusoidal illumination?

## Discussion.

(a) Constant illumination. If $g_{L}(t)$ is a constant,

$$
\begin{equation*}
g_{L}(t)=G \tag{3.36}
\end{equation*}
$$

then the particular solution for $n^{\prime}(t)$ is also a constant,

$$
\begin{equation*}
n^{\prime}(t)=G \tau_{e} \tag{3.37}
\end{equation*}
$$

The total solution is then $n^{\prime}(t)=G \tau_{e}+A e^{-t / \tau_{e}}$, where we still need to find $A$. In this case, if we assume that the illumination has been on for a very long time, we know that all transients (i.e., all remnants of the homogeneous solution) must have died out and thus $A$ must be zero. In terms of an initial condition, we are saying that the excess population must remain finite, and unless $A$ is zero, $n^{\prime}(t)$ would become infinite in the limit of $t \rightarrow-\infty$.

We have found that $n^{\prime}(t)$ is $G \tau_{e}$ in a uniform sample under steady illumination generating $G$ hole-electron pairs uniformly throughout its bulk, but we are not done yet. We got our solution under the assumption of low-level injection, and we must check that that assumption was valid. Thus we must confirm that $G \tau_{e} \ll p_{o}$. If it is, we are done. If it is not, we must go back and solve Eq. (3.28), rather than using Eq. (3.33).
(b) Step-on, step-off illumination. Now imagine that our $p$-type sample is in thermal equilibrium for $t<0$; at $t=0$ a steady illumination creating $g_{L}(t)=G$ is turned on, and then at $t=T$, where $T>0$, the illumination is turned off. This is illustrated in Fig. 3.3a.

For $t<0, n^{\prime}(t)=p^{\prime}(t)=0$. This is our initial condition on $n^{\prime}(t)$ at $t=0$. To reach this conclusion it is important to realize that we have implicitly used the constraint that according to Eq. (3.33), $n^{\prime}(t)$ must be continuous and cannot change instantaneously-that is, $d n^{\prime} / d t$ must be finite-unless $g_{L}(t)$ is infinite. Since $g_{L}(t)$ is not infinite in this example, we must have $n^{\prime}(0)=0$.

For $0 \leq t \leq T$, the particular solution is again $G \tau_{e}$ and we have

$$
\begin{equation*}
n^{\prime}(t)=G \tau_{e}+A e^{-t / \tau_{e}} \quad \text { for } 0 \leq t \leq T \tag{3.38}
\end{equation*}
$$

subject to the initial condition $n^{\prime}(0)=0$. Imposing this condition, we see that $A$ is $-G \tau_{e}$ and thus

$$
\begin{equation*}
n^{\prime}(t)=G \tau_{e}\left(1-e^{-t / \tau_{e}}\right) \quad \text { for } 0 \leq t \leq T \tag{3.39}
\end{equation*}
$$

For $T \leq t, g_{L}(t)$ is again zero, and thus the particular solution is also zero. Then the total solution is just the homogeneous solution, Eg. (3.35), with A chosen to satisfy the initial condition. The initial condition is

$$
\begin{equation*}
n^{\prime}(T)=G \tau_{e}\left(1-e^{-T / \tau_{e}}\right) \tag{3.40}
\end{equation*}
$$

We find

$$
\begin{equation*}
n^{\prime}(t)=G \tau_{e}\left(1-e^{-T / \tau_{e}}\right) e^{-(t-T) / \tau_{e}} \quad \text { for } T \leq t \tag{3.41}
\end{equation*}
$$

This solution is illustrated in Fig. $3.3 b$ for a situation where $T$ and $\tau_{e}$ are comparable.


FIGURE 3.3
Step-on, step-off illumination: (a) the generation term $g_{L}(f) ;(b)$ the excess minority carrier concentration $n^{\prime}(t)$ for $\tau_{e} \approx T$; (c) $n^{\prime}(t)$ for $\tau_{e} \ll T$; and (d) $n^{\prime}(t)$ for $\tau_{e} \gg T$.

It is worthwhile to consider two other extremes of $T$ : when $T \gg \tau_{e}$ and when $T \ll \tau_{e}$. In the first case, the transient will have died out by the time the illumination is turned off, and for $t \geq T$ we will find

$$
\begin{equation*}
n^{\prime}(t) \approx G \tau_{e} e^{-(t-T) / \tau_{e}} \quad \text { for } T \leq t \tag{3.42}
\end{equation*}
$$

This is illustrated in Fig. 3.3c.
When $T \ll \tau_{e}$, the exponential factor in the solution for $0<t<T$, that is, Eq. (3.35), will always be small and we can approximate the term using $\left(1-e^{-x}\right) \approx x$ when $x \ll 1$. Thus

$$
\begin{equation*}
n^{\prime}(t) \approx G t \quad \text { for } 0 \leq t \leq T \tag{3.43}
\end{equation*}
$$

and

$$
\begin{equation*}
n^{\prime}(t) \approx G T e^{-(t-T) / \tau_{e}} \quad \text { for } T \leq t \tag{3.44}
\end{equation*}
$$

This solution is illustrated in Fig. 3.3d.
In all of these cases, we would of course have to verify that low-level injection was not violated before we could say that we were truly done solving the problem.
(c) Square wave illumination. Next consider that the illumination is turned on and off regularly for equal amounts of time, $T / 2$, and that this process has been continuing for a very long time, so that a steady state has been reached. The corresponding $g_{L}(t)$ is illustrated in Fig. 3.4a. The boundary condition in this case is that $n^{\prime}(t)$ must be repetitive, that is, that $n^{\prime}(t+T)=n^{\prime}(t)$. We can also simplify the task of finding $n^{\prime}(t)$ if we use the fact that we have a linear system. We know then that the average of the response will be the same as the response to the average input. The average of the excitation is $G / 2$ so the average of the excess population should be $G \tau_{e} / 2$. Also, since the excitation is symmetrical about its average value, the response should also be symmetrical about its average value. With these suggestions you should be able to complete the solution yourself; the results for $T \approx \tau_{e}, T \gg \tau_{e}$, and $T \ll \tau_{e}$ are illustrated in Figs. 3.4b, $c$, and $d$, respectively.
(d) Steady sinusoidal illumination. If $g_{L}(t)$ is varying sinusoidally with frequency $\omega$, and the illumination has been on for a very long time before $t=0$, we have

$$
\begin{equation*}
g_{L}(t)=G(1+\cos \omega t) \tag{3.45}
\end{equation*}
$$

Notice we must always have $g_{L} \geq 0$, so we must add a steady illumination $G$, to the sinusoidal term. Nonetheless, we can mathematically solve for $n^{\prime}(t)$ using a $g_{L}(t)$ that becomes negative; that is, we can use superposition and solve for $n^{\prime}(t)$ due to $G$ and for $n^{\prime}(t)$ due to $G \cos \omega t$ and combine these results to obtain $n^{\prime}(t)$ due to $G+G \cos \omega t$, which is our actual $g_{L}(t)$.

We know that the excess population due to $G$ is $G \tau_{e}$. We thus need to find only $n^{\prime}(t)$ due to $G \cos \omega t$. There are two ways we might proceed. The first is to realize that the solution will be of the form $B \cos (\omega t+\theta)$, substitute this form into Eq. (3.33), and solve for $B$ and $\theta$. The second is to recognize $G \cos \omega t$ as the real part of $G e^{j \omega t}$. The particular solution for this later excitation is of the form $B e^{j(\omega t+\theta)}$, and the solution we seek is $\operatorname{Re}\left[B e^{j( }(\omega t+\theta)\right]$.



(c)


FIGURE 3.4
Square wave illumination: (a) the generation term $g_{L}(t) ;(b)$ the excess minority carrier concentration $n^{\prime}(t)$ for $\tau_{e} \approx T$; (c) $n^{\prime}(t)$ for $\tau_{e} \ll T$; and (d) $n^{\prime}(t)$ for $\tau_{e} \gg T$.

Proceeding by either of these routes, the details of which are left as an exercise, we obtain

$$
\begin{equation*}
B=\frac{G \tau_{e}}{\sqrt{1+\omega^{2} \tau_{e}^{2}}} \quad \text { and } \quad \theta=-\tan ^{-1}\left(\omega \tau_{e}\right) \tag{3.46}
\end{equation*}
$$

Clearly, when $\omega \tau_{e} \ll 1$, the response "tracks" the excitation, and when $\omega \tau_{e} \gg$ 1 , the response is a small variation about the average value $90^{\circ}$ out of phase with, and behind, the excitation. These results are summarized in Fig. 3.5. You may wish to compare these results with what we found for a square wave excitation, Fig. 3.4.

### 3.2.3 High-Level Injection Populations and Transients

When low-level injection conditions are no longer met we must deal with the nonlinear differential equation, Eq. (3.28), which we rewrite here using our definition of $\tau_{\min }$ to replace $r$ :

$$
\frac{d n^{\prime}}{d t}=g_{L}(t)-\frac{n^{\prime}}{\tau_{\min }}-\frac{\left(n^{\prime}\right)^{2}}{\left(p_{o}+n_{o}\right) \tau_{\min }}
$$

As we noted earlier, this equation is in general difficult to solve, but there are two important special problems for which we can get solutions: (1) the steady-state population under constant illumination, $g_{L}(t)=G$; and (2) the initial population transient after extinction of intense illumination.
a) Constant illumination. With steady illumination, $g_{L}(t)=G$, the time derivative of the population is zero in the steady state and the excess population, which we will label $N^{\prime}$, satisfies

$$
\begin{equation*}
\frac{N^{\prime 2}}{\left(p_{o}+n_{o}\right) \tau_{\min }}+\frac{N^{\prime}}{\tau_{\min }}-G=0 \tag{3.47a}
\end{equation*}
$$

or, rearranging factors,

$$
\begin{equation*}
N^{\prime 2}+\left(p_{o}+n_{o}\right) N^{\prime}-G\left(p_{o}+n_{o}\right) \tau_{\min }=0 \tag{3.47b}
\end{equation*}
$$

Solving this quadratic, we find

$$
\begin{equation*}
N^{\prime}=\frac{\left(p_{o}+n_{o}\right)}{2}\left[\sqrt{1+\frac{4 G \tau_{\min }}{\left(p_{o}+n_{o}\right)}}-1\right] \tag{3.48a}
\end{equation*}
$$

You can easily confirm that this result reduces to Eq. (3.37) when $G \tau_{\min }$ is much less than $\left(p_{o}+n_{o}\right)$, which corresponds to low-level injection. You should also note that $N^{\prime}$ is always less than $G \tau_{\min }$, a fact you can see by rearranging Eq. (3.47a). You may want to think about the significance of this observation-does it make intuitive sense?


FIGURE 3.5
Sinusoidal illumination: (a) the generation term $g_{L}(t)$; $(b)$ the excess minority carrier concentration $n^{\prime}(t)$ for $\omega t_{e} \ll 1 ; n^{\prime}(t)$ for $(c) \omega \tau_{e} \approx 1$; and $n^{\prime}(t)$ for $(d) \omega \tau_{e} \gg 1$.

Finally, you should notice that in the limit of $G$ being much greater than $\left(p_{o}+n_{o}\right) / \tau_{\min }, N^{\prime}$ is given by

$$
\begin{equation*}
N^{\prime} \approx \sqrt{G \tau_{\min }\left(p_{o}+n_{o}\right)} \tag{3.48b}
\end{equation*}
$$

Note that $N^{\prime}$ increases only as $\sqrt{G}$ in this extreme, rather than as $G$, as it does in low-level injection.
b) Initial decay transient. In the preceding section we found the steady-state carrier population under constant intense illumination. In this section we address the question of how rapidly this population decays (i.e., decreases) when this intense illumination is extinguished. To answer this question we can find the homogeneous solution to Eq. (3.28') when the $\left(n^{\prime}\right)^{2}$ term is dominant, that is, when $n^{\prime} \gg\left(p_{0}+n_{0}\right)$. Thus we want the solution to

$$
\begin{equation*}
\frac{d n^{\prime}}{d t}+\frac{\left(n^{\prime}\right)^{2}}{\left(p_{o}+n_{o}\right) \tau_{\min }}=0 \tag{3.49}
\end{equation*}
$$

subject to the initial condition that $n^{\prime}(0)$ is given by Eq. (3.48b). This solution is

$$
\begin{equation*}
n^{\prime}(t)=\frac{n^{\prime}(0)}{1+\left[n^{\prime}(0) t /\left(p_{o}+n_{o}\right) \tau_{\min }\right]} \tag{3.50a}
\end{equation*}
$$

For $t \gg\left(p_{o}+n_{o}\right) \tau_{\min } / n^{\prime}(0)$, the 1 in the above denominator can be neglected and we have essentially

$$
\begin{equation*}
n^{\prime}(t) \approx \frac{\left(p_{o}+n_{o}\right) \tau_{\min }}{t} \tag{3.50b}
\end{equation*}
$$

that is, $n^{\prime}(t)$ varies inversely with $t$.
These expressions are valid as long as $n^{\prime}(t)$ is much greater than $\left(p_{o}+n_{o}\right)$, that is, as long as $t$ is much less than $\tau_{\min }$.

An interesting question to ask is whether the rate of decay of the excess population is faster or slower after excitation to high-level injection (HLI) conditions than it is after low-level injection (LLI) excitation. To examine this question we turn to Eqs. (3.33) and (3.49), and use them to evaluate the rate of change of $n^{\prime}$ at $t=0^{+}$. Upon doing this we find that the initial rates of decay in LLI, $n^{\prime} \ll\left(p_{o}+n_{o}\right)$, are

$$
\begin{equation*}
\left.\frac{d n^{\prime}}{d t}\right|_{t=0^{+}}=-\frac{n^{\prime}(0)}{\tau_{\min }} \tag{3.51a}
\end{equation*}
$$

and in HLI, $n^{\prime} \gg\left(p_{o}+n_{o}\right)$, they are

$$
\begin{equation*}
\left.\frac{d n^{\prime}}{d t}\right|_{t=0^{+}}=-\frac{n^{\prime}(0)^{2}}{\left(p_{o}+n_{o}\right) \tau_{\min }} \tag{3.51b}
\end{equation*}
$$

Not surprisingly, in both cases increasing the initial population $n^{\prime}(0)$, increases the absolute rate of decay, and the HLI case indeed decays more rapidly. A more meaningful quantity to consider, however, is the rate of decay normalized to the
initial population, rather than the absolute rate; that is, $d n^{\prime} / d t$ divided by $n^{\prime}$, rather than just $d n^{\prime} / d t$. Upon dividing the above expressions by $n^{\prime}(0)$ we find that the normalized rates in LLI are

$$
\begin{equation*}
\left.\frac{d n^{\prime} / d t}{n^{\prime}}\right|_{t=0^{+}}=-\frac{1}{\tau_{\min }} \tag{3.52a}
\end{equation*}
$$

and in HLI they are

$$
\begin{equation*}
\left.\frac{d n^{\prime} / d t}{n^{\prime}}\right|_{t=0^{+}}=-\frac{n^{\prime}(0)}{\left(p_{o}+n_{o}\right) \tau_{\min }} \tag{3.52b}
\end{equation*}
$$

When the equations are written in this way we see clearly that the normalized decay rate is independent of the pumping level as long as LLI conditions are maintained, whereas when a sample is pumped to HLI the normalized decay rate is much larger and varies in direct proportion to the excess population.

### 3.3 PHOTOCONDUCTIVITY AND PHOTOCONDUCTORS

Thus far in this chapter we have considered the individual effects of a uniform electric field and uniform optical excitation on a uniformly doped semiconductor. If we now consider applying a uniform electric field to a uniform semiconductor that is uniformly excited optically, we discover a phenomenon called photoconductivity; we also have the essential ingredients of a device called the photoconductor, which can electrically detect, or "sense," the presence of light. As we shall see, photoconductors are extremely simple devices, and historically they were some of the first successful semiconductor devices. Cadmium sulfide (CdS) photoconductors, for example, have for years been used in light meters for photography. In spite of the long history of photoconductor design, innoyations still continue. Some of the fastest semiconductor switches ever made use gallium arsenide ( GaAs ) photoconductors fabricated using state-of-the-art processing technologies.

In this section we will look first at the basic phenomenon of photoconductivity and then we will turn to specific issues relevant to the design of photoconductors for particular applications.

### 3.3.1 Basic Concepts

The idea of photoconductivity is that simply illuminating a semiconductor sample increases the carrier concentration in that sample and this, in turn, increases its conductivity. This optically induced conductivity is called photoconductivity.

Quantitatively, we know that the conductivity is in general given by

$$
\begin{equation*}
\sigma=q\left[\mu_{e} n+\mu_{h} p\right] \tag{3.53a}
\end{equation*}
$$

Writing this specifically in terms of the equilibrium and excess populations, we have

$$
\begin{equation*}
\sigma=q\left[\mu_{e}\left(n_{o}+n^{\prime}\right)+\mu_{h}\left(p_{o}+p^{\prime}\right)\right] \tag{3.53b}
\end{equation*}
$$

From this expression we can identify the thermal equilibrium conductivity $\sigma_{o}$ as

$$
\begin{equation*}
\sigma_{o}=q\left[\mu_{e} n_{o}+\mu_{h} p_{o}\right] \tag{3.54}
\end{equation*}
$$

and the excess conductivity, or photoconductivity, $\sigma^{\prime}$ as

$$
\begin{equation*}
\sigma^{\prime}=q\left[\mu_{e} n^{\prime}+\mu_{h} p^{\prime}\right] \tag{3.55a}
\end{equation*}
$$

Since holes and electrons are generated in pairs, $n^{\prime}=p^{\prime}$ and we have

$$
\begin{equation*}
\sigma^{\prime}=q\left(\mu_{e}+\mu_{h}\right) n^{\prime} \tag{3.55b}
\end{equation*}
$$

We already know how to calculate $n^{\prime}$ for a semiconductor sample given the generation function, so we can easily calculate the change in conductivity, $\sigma^{\prime}$, corresponding to particular illumination conditions.

We next consider the design of devices that are optimized to use the phenomenon of photoconductivity to detect light.

### 3.3.2 Specific Device Issues

As a practical matter the fractional change in conductivity represented by Eq. (3.55b) is in general small if the hole and electron mobilities are comparable and if the excitation is low-level injection. If one wants simply to detect the presence or absence of light, one solution to this problem is to use a very lightly doped piece of semiconductor and excite it to high-level injection conditions. The unilluminated device will then have a very high resistance, and the illumination will make the resistance much smaller. This change will be easily detectable, and such a device will make a good light-activated switch.

In many situations, however, it is desirable to have a sensor with a response that is linearly proportional to the intensity of the illumination. For such applications we must restrict ourselves to semiconductors operating under lowlevel injection conditions (to see this, refer to Eqs. (3.37) and (3.48) for $n^{\prime}$ as a function of $G$ with constant LLI and HLI excitation, respectively). The type of device described in the previous paragraph is not particularly useful for this type of application.

An interesting solution to the dilemma of achieving a large fractional change in conductivity while still retaining LLI conditions, has been to develop materials for use in photoconductors for which the majority carriers have effectively zero mobility and the minority carriers have a normally high mobility. In such a photoconductor (i.e., one in which, for example, $\mu_{h} \approx 0$ ) we have no conductivity in the absence of light (i.e., $\sigma_{o} \approx 0$ ) whereas under illumination we find $\sigma \approx q \mu_{e} n^{\prime}$, assuming the majority carriers are holes.

The situation we have just described can be achieved by having a concentration, $N_{a}$ of shallow acceptors and a larger concentration $N_{t}$ of relatively deep donors, where "relatively deep" means that the donor energy $E_{t}$ is such that ( $E_{c}-E_{t}$ ) is many times $k T / q$. This situation is illustrated in Fig. 3.6 in terms of our energy pictures of Chap. 2.


FIGURE 3.6
Relative positions on an electron energy scale of the possible sites for electrons in a photoconductor containing deep donors and shallow acceptors.

Because the donors have been selected so that $\left(E_{c}-E_{t}\right)$ is much greater than $k T / q$, it is unlikely that electrons will be thermally excited from these deep donors, which we call traps, into conduction states and so $n_{o}$ will be very small. However, even though these deep donors do not become thermally ionized with the creation of conduction electrons, $N_{a}$ of them are nonetheless ionized because they provide electrons to fill the $N_{a}$ acceptor states. Denoting the equilibrium density of ionized traps as $N_{t o}^{+}$, we thus have

$$
\begin{equation*}
N_{t o}^{+}=N_{a} \tag{3.56}
\end{equation*}
$$

These $N_{a}$ ionized trap states play the role of the majority hole carriers in our discussion and clearly have zero mobility because they can't move.

When electrons are optically excited from the bonding states to the conduction states in such a sample (i.e., when a mobile electron and a mobile hole are created) an electron from a trap level very quickly recombines with the hole, leaving behind an additional ionized trap. The net effect of the light is then to create excess mobile, negatively charged conduction electrons and excess fixed, positively charged ionized traps, rather than excess mobile, positively charged holes. If we denote the excess density of ionized traps as $N_{t}^{+}$, we have

$$
n^{\prime}=N_{t}^{+}
$$

The equivalent of the low-level injection restriction is now that these excesses be much less than $N_{\text {to }}^{+}$. Since we have said that $N_{\text {to }}^{+}$is equal to $N_{a}$, we
thus want to have $n^{\prime} \ll N_{a}$. When this is the case, $n^{\prime}$ is a linear function of $g$ and it satisfies Eq. (3.33), which we repeat here:

$$
\begin{equation*}
\frac{d n^{\prime}}{d t}+\frac{n^{\prime}}{\tau_{\min }}=g_{L}(t) \tag{3.33}
\end{equation*}
$$

The value of $\tau_{\min }$ appropriate to the sample in question must, of course, be used. Physically this lifetime corresponds to the rate at which the conduction electrons reoccupy the ionized trap levels.

A second issue that arises in photoconductor design concerns the fact that it is desirable to have the light absorbed completely in the device so as to generate the largest possible number of carriers and make the largest possible change in conductivity. However, if all of the light is to be absorbed, the generation function cannot simultaneously be constant (i.e., uniform) throughout the thickness of the device. Instead, $g_{L}$ must decrease moving in from the surface as the illuminating radiation is absorbed and its intensity decreases. We can model the interaction of light with an absorbing solid in terms of an absorption coefficient. We say that the rate at which absorption occurs and thus at which the intensity decreases is proportional to the intensity; the constant of proportionality is the absorption coefficient $\alpha$. Assuming the light is propagating in the $x$-direction and denoting the intensity as $L$, which has the units photons $/ \mathrm{cm}^{2} \cdot \mathrm{~s}$, we have

$$
\begin{equation*}
\frac{d L}{d x}=\alpha L \tag{3.57}
\end{equation*}
$$

where $\alpha$ has the units $\mathrm{cm}^{-1}$. Solving this equation yields

$$
\begin{equation*}
L(x)=L_{0} e^{-\alpha x} \tag{3.58}
\end{equation*}
$$

where we have assumed that the absorbing solid occupies the region $x>0$ and that the light is incident from the left with an intensity $L_{0}$ at $x=0$. This situation is illustrated in Fig. 3.7.

If each photon that is absorbed creates one hole-electron pair, the generation function $g$ will be $\alpha L$, which is clearly a function of $x$. This violates our basic assumption in this chapter that we have uniform excitation. Interestingly, however, in a situation like that illustrated in Fig. 3.7, in which the electric field and conduction are normal to the direction of incidence of the light and thus normal to the nonuniformity, we can still get a solution. The key is that the sample can be thought of as an infinite number of infinitesimally thin slabs, each with thickness $d x$ and each with a mobile carrier concentration $n^{\prime}(x)$. The conductance of each slab $W$ wide, $D$ long, and $d x$ thick is $q \mu_{e} n^{\prime}(x) W d x / D$; and the total conductance of the sample is the sum of all these slab conductances because they are connected electrically in parallel. Thus

$$
\begin{equation*}
G^{\prime}=q \frac{\mu_{e} W}{D} \int_{0}^{T} n^{\prime}(x) d x \tag{3.59}
\end{equation*}
$$

From this result we see that what matters is the total number of excess carriers per unit area normal to the surface, not their detailed distribution. Thus even if


FIGURE 3.7
(a) Representative photoconductor; (b) variation of the light intensity with position into the structure. It has been assumed in this plot that there is negligible reflection at the interfaces in the structure, and that the absorption coefficient $\alpha$ is comparable to $1 / T$.
the excess carriers move in the $x$-direction away from the point where they are created (as the next chapter shows they will), the sample's conductance is not changed.

If we restrict ourselves to low-level injection conditions, the rate at which the excess carriers recombine in the sample is similarly independent of their position in the $x$-direction. To see this we recall that the recombination per unit volume in any plane is $n^{\prime} / \tau_{\min }$. Thus the total recombination rate in the sample is $W D \int_{0}^{T} n^{\prime}(x) d x / \tau_{\min }$. Because this result depends only on the integral of $n^{\prime}$, not on the detailed distribution, the total recombination and hence the total excess population will not be changed if the carriers move around.

Because the final answer is not affected by where the carriers are normal to the surface, we can proceed by again imagining the sample to be divided into thin slabs that are isolated so that the carriers cannot move up or down from one slab to the next. In such a situation, $n^{\prime}$ in each slab is $\tau_{\min } g$. If we then have a constant low-level illumination $L_{0}$ incident on the top surface of the sample, $g$ is $\alpha L(x)$, where $L(x)$ is given by Eq. (3.58), and thus $n^{\prime}(x)$ is $\tau_{\min } \alpha L_{0} e^{-\alpha L}$. Substituting this in Eq. (3.59) we have

$$
\begin{equation*}
G^{\prime}=q \frac{\mu_{e} W}{D} \tau_{\min } \alpha L_{0} \int_{0}^{T} e^{-\alpha(x)} d x \tag{3.60a}
\end{equation*}
$$

which gives us

$$
\begin{equation*}
G^{\prime}=q \frac{\mu_{e} W \tau_{\min } L_{0}}{D}\left(1-e^{-T \alpha}\right) \tag{3.60b}
\end{equation*}
$$

This result teaches us that it is advantageous to have $T \gg 1 / \alpha$ so that the factor $e^{-T \alpha}$ is essentially zero and $G^{\prime}$ is as large as possible.

This completes our discussion of photoconductors.

### 3.4 SUMMARY

In this chapter we have looked at two important ways of exciting a semiconductor: electrically and optically.

Applying a uniform electric field led us to consider a form of carrier motion we call drift, which we model with the concepts of mobility and conductivity. Charge carriers in a solid under the influence of a moderate uniform static electric field attain a net average velocity proportional to that field:

$$
\bar{s}_{x}= \pm \mu_{I} \mathscr{E}_{x}
$$

where the sign assumed is the same as that of the charge on the carriers. This net velocity results in a net motion of charge (i.e., a current density) proportional to the electric field. In a semiconductor with two carrier types, holes and electrons, the drift current density is

$$
J_{x}=q\left(n_{o} \mu_{e}+p_{o} \mu_{h}\right) \mathscr{E}_{x}
$$

The factor of proportionality between the electric field and drift current density is called the conductivity, which in a semiconductor is given by

$$
\sigma=q\left(n_{o} \mu_{e}+p_{o} \mu_{h}\right)
$$

Applying uniform optical excitation to a semiconductor led us to a nonlinear differential equation for the carrier concentrations, but we found that restricting the excitation to low levels of injection allowed us to linearize the problem. We introduced the concepts of excess carriers, low-level injection, and minority carrier lifetime to model this problem, and showed that under low-level conditions (i.e., $n^{t} \ll p_{o}$ ) the excess minority carrier concentration obeyed the following equation (we assume $p$-type here):

$$
\frac{d n^{\prime}}{d t}+\frac{n^{\prime}}{\tau_{\min }}=g_{L}(t)
$$

The homogeneous solution of this equation has the form $e^{-t / \tau_{\min }}$, from which we saw that the minority carrier lifetime is the natural response time of the system. The particular solution depends on the form of the optical excitation. Several common forms were considered as examples, and we saw that, as expected, the
excess minority carrier concentration will follow, or "track," changes in $g_{L}(t)$ occurring slowly (on a time scale of $\tau_{\min }$ ) but will lag behind more rapid changes.

Finally, we considered the simultaneous application of optical and electric field excitation to a semiconductor and introduced the concept of photoconductivity, which is the change of the conductivity of a semiconductor sample under the influence of light. This modulation forms the basis of an important class of optical sensors called photoconductors. Photoconductors can be designed and used either as optically activated switches or as linear sensors of light intensity. In the latter case, we saw how, by the introduction of deep donors, semiconductor materials can be engineered to have a large conductivity change even under low-level injection conditions.

## PROBLEMS

3.1 What is the conductivity of the following semiconductor samples at room temperature, assuming $\mu_{e}=1500 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}$ and $\mu_{h}=600 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}$ ?
(a) $n_{0}=4 \times 10^{16} \mathrm{~cm}^{-3}, p_{0}=5 \times 10^{3} \mathrm{~cm}^{-3}$
(b) $n_{o}=2 \times 10^{3} \mathrm{~cm}^{-3}, p_{o}=1 \times 10^{17} \mathrm{~cm}^{-3}$
(c) $n_{0}=p_{0}=1 \times 10^{10} \mathrm{~cm}^{-3}$
3.2 Consider a sample of germanium with $3 \times 10^{15} \mathrm{~cm}^{-3}$ gallium atoms. Determine the following quantities at room temperature for this sample.
(a) Majority carrier type
(b) Majority carrier concentration
(c) Minority carrier concentration
(d) Conductivity
(e) Repeat parts (a) thru (d) assuming that in addition to the $3 \times 10^{15} \mathrm{~cm}^{-3}$ gallium atoms, there are also $1 \times 10^{16} \mathrm{~cm}^{-3}$ arsenic atoms in the sample.
3.3 (a) Calculate the root-mean-square velocity of an electron in silicon at room temperature, assuming it has a thermal kinetic energy $m^{*} s^{2} / 2$ equal to $3 k T / 2$, where $k T$ is 0.025 eV . The effective mass $\mathrm{m}^{*}$ of an electron in silicon is about 26 percent that of an electron in free space and can be taken to be $2 \times 10^{-31} \mathrm{~kg}$. (Be careful with your units.)
(b) Calculate the average net velocity of an electron in silicon moving under the
(c) Compare your answers in (a) and (b) and comment on what you see.
3.4 (a) Consider a sample of $n$-type silicon $L \mathrm{~cm}$ long, $W \mathrm{~cm}$ wide, and $T \mathrm{~cm}$ thick that is nonuniformly doped in such a manner that the equilibrium majority carrier population varies throughout its thickness as $n_{o}(x)$ (see Fig. P3.4a). Show that if the mobility $\mu_{e}$ is constant, independent of the doping level, then the end-to-end resistance of this sample depends only on the integral of $n_{0}(x)$ over the thickness of the sample (i.e., from $x=0$ at the top surface to $x=T$ at the bottom surface) and not on the actual shape of $n_{o}(x)$. (Hint: Mentally divide the sample into thin slabs of material $d x$ thick, and add the conductances of these slabs connected parallel.)
(b) In an integrated circuit, dopants are introduced to the top surface of a silicon wafer (slab) to produce nonuniformly doped regions like the sample described in (a) and resistors are formed by putting contacts at the ends of rectangularly


FIGURE P3.4a
shaped regions doped in this manner. Suppose that the doping profile of such a resistive region is such that

$$
n_{o}(x)=10^{18} e^{-x / X} \mathrm{~cm}^{-3}
$$

where $X$ is $2 \mu \mathrm{~m}$. Assume $\mathrm{T} \gg 2 \mu \mathrm{~m}$. What resistance would a square region with this profile, $L$ units by $L$ units in size, have? This resistance is called the sheet resistance, $\mathrm{R}_{\mathrm{s}}$, of the region. (Note: $1 \mu \mathrm{~m}=10^{-4} \mathrm{~cm}$.)
(c) The dopant profile in part (b) is introduced in a pattern like that illustrated in Fig. P3.4c. What is the approximate resistance between points $A$ and $B$ of this resistor?


FIGURE P3.4c
3.5 (a) Calculate the mobility of electrons in aluminum at room temperature using the following data and assuming that there is one conduction electron per atom.

| Resistivity of aluminum | $2.8 \times 10^{-6} \Omega \cdot \mathrm{~cm}$ |
| :--- | :--- |
| Density of aluminum | $2.7 \mathrm{gm} / \mathrm{cm}^{3}$ |
| Atomic weight of A1 | $27 \mathrm{gm} / \mathrm{mole}$ |
| Avogadro's number | $6 \times 10^{23} \mathrm{~mole}^{-1}$ |

(b) Compare your answer from part (a) to the mobility of electrons in silicon. What does the difference indicate to you?
3.6 The conductivity of copper is approximately $6 \times 10^{5} \mathrm{mho} / \mathrm{cm}$ at room temperature and is due to the mobility of electrons (one per atom) free to move under the influence of an electric field. The concentration of these conduction electrons is approximately $10^{23} \mathrm{~cm}^{-3}$.
(a) Calculate the electron mobility in copper at room temperature. How does this compare with Si and Ge ?
(b) Calculate the net average velocity of the electrons in the direction of the current flow (assume it is the $x$-direction) in a $0.1-\mathrm{mm}^{2}$ cross-sectional area wire carrying a current of 1 A . [Assume that the current is due to the cooperative motion of the electrons ("drift") superimposed on their random thermal velocity (which by itself does not lead to any net current).]
3.7 A sample of silicon uniformly doped with $2 \times 10^{16} \mathrm{~cm}^{-3}$ donors is illuminated by penetrating light that generates $10^{20}$ hole-electron pairs per second per $\mathrm{cm}^{3}$ uniformly throughout its bulk. The conductivity of the sample is found to increase by 1 percent (i.e., from $\sigma_{o}$ to $1.01 \sigma_{o}$ ) when it is illuminated. You may use $\mu_{e}=1500 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}$, $\mu_{h}=600 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}$, and $n_{i}(300 \mathrm{~K})=1.0 \times 10^{10} \mathrm{~cm}^{-3}$.
(a) Calculate $n_{0}, p_{o}$, and $\sigma_{0}$.
(b) What are $n^{\prime}$ and $p^{\prime}$ ?
(c) Do low-level injection conditions hold? Why?
(d) What is the minority carrier lifetime $\tau_{h}$ ?
(e) How does the conductivity vary with time if, after being on for a long time, the illumination is extinguished at $t=0$ ?
3.8 Consider a uniformly doped germanium sample with reflecting boundaries in which the minority carrier lifetime $\tau_{m}$ is $10^{-3} \mathrm{~s}$. The sample is illuminated by steady-state light generating $G$ hole-electron pairs $/ \mathrm{cm}^{3}$.s uniformly throughout its bulk, with the result that everywhere $n=n_{o}+n^{\prime}=5 \times 10^{16} \mathrm{~cm}^{-3}$ and $p=p_{o}+p^{\prime}=10^{13} \mathrm{~cm}^{-3}$. Assume that for germanium at room temperature $\mu_{e}=3900 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}, \mu_{h}=1900$ $\mathrm{cm}^{2} / \mathrm{V} \cdot \mathrm{s}$, and $n_{i}=2.4 \times 10^{13} \mathrm{~cm}^{-3}$.
(a) Calculate the thermal equilibrium electron and hole concentrations $n_{0}$ and $p_{0}$ in this sample.
(b) Calculate the excess electron and hole concentrations $n^{\prime}$ and $p^{\prime}$ in this sample when it is illuminated by $g_{L}=G$.
(c) Calculate the optical generation intensity $G$.
(d) Calculate the resistivity of this sample.
(e) After the illumination has been on for a very long time, its intensity is abruptly cut in half. Assuming that this occurs at $t=0$, that is,

$$
\dot{g}_{L}(t)=G \quad \text { for } \quad t<0 \quad \text { and } \quad g_{L}(t)=\frac{G}{2} \quad \text { for } \quad t \geq 0
$$

find an expression for $p^{\prime}(t)$ valid for $t \geq 0$.


FIGURE P3.9


FIGURE P3.9e
3.9 A uniformly doped $p$-type germanium sample, $p_{o}=10^{17} \mathrm{~cm}^{-3}$, is illuminated such that the generation function, $g_{l}(t)$, varies with time as illustrated in Fig. P3.9.

The minority carrier lifetime in this sample is $\tau_{e}$. You may assume that lowlevel injection is maintained.
(a) What is $n^{\prime}(t)$ for $0 \leq t \leq T$ ?
(b) If the excess minority carrier population at $t=T$ is $n^{\prime}(T)$, what is the population as a function of time for $t \geq T$ ?
(c) Find a linear expression for $n^{\prime}(t)$ in the range $0 \leq t \leq T$ valid when $T \ll \tau_{e}$.
(d) What is $n^{\prime}(T)$ in the limit $T \ll \tau_{e}$ ?
(e) The generation function is changed to that indicated in Fig. P3.9e. In the limit $T \ll \tau_{e}$, what is $n^{\prime}(T)$ for this excitation. What is $n^{\prime}(t)$ for $t>T$ ?
3.10 A sample of germanium which is uniformly doped with $5 \times 10^{16} \mathrm{~cm}^{-3}$ boron atoms and in which the minority carrier lifetime is $10^{-4} \mathrm{~s}$ is illuminated with light, generating hole-electron pairs uniformly throughout it with a repetitive time variation illustrated in Fig. P3.10. Assume that the illumination has been on for a long time and that the quantity $a$ is a constant between 0 and 0.5 , that is, $0<a<0.5$.
(a) Sketch and dimension the excess minority carrier concentration for one period in the steady state in the case where the product $a T$ is much greater than the minority carrier lifetime, that is, when $a T \gg 10^{-4} \mathrm{~s}$.


FIGURE P3. 10
(b) What is the time-average value over many periods of the excess minority carrier concentration? Your answer should be given in terms of $G$ and $a$. Remember that this is a linear problem.
(c) Sketch and dimension the excess minority carrier concentration for one period in the steady state in the case where $T \ll 10^{-4} \mathrm{~s}$ and $a=0.25$.
3.11 Consider a uniformly doped sample of extrinsic $p$-type silicon with a minority carrier lifetime $\tau_{e}$. Suppose that this sample is illuminated by light that generates holeelectron pairs uniformly throughout its bulk as

$$
g_{L}(t)=G_{L}+g_{l}(t)
$$

$G_{L}$ is not a function of time and is of sufficient magnitude that it violates low-level injection conditions, and $g_{l}(t)$ is time-dependent and does not alone violate lowlevel injection. When $G_{L}$ alone is illuminating the sample, call the excess electron population $n_{1}^{\prime}$; when $g_{l}(t)$ alone is illuminating the sample, call it $n_{2}^{\prime}$; and when $g_{L}$ ( $=G_{L}+g_{l}$ ) is illuminating the sample, call it $n_{3}^{\prime}$.
(a) Find the quadratic equation that must be solved to find $n_{1}^{\prime}$ in terms of $\tau_{e}, G_{L}$, and $p_{o}$. (This was done in the text, but go through it yourself.)
(b) Show that $n^{\prime} 3$ can be written as $n^{\prime}{ }_{3}=n_{1}+n_{4}^{\prime}$ where $n_{4}{ }_{4}$ satisfies the differential equation

$$
\frac{d n_{4}^{\prime}}{d t}=g_{l}(t)-\frac{n_{4}^{\prime}}{\tau^{\prime}}
$$

(c) Find an expression for $\tau^{\prime}$, argue that it is reasonable physically (i.e., that it looks "right"), and explain why.
(d) Is $n_{2}^{\prime}=n_{4}^{\prime}$ ? Explain your answer.
3.12 Consider an $n$-type sample of gallium arsenide with $N_{D}=5 \times 10^{16} \mathrm{~cm}^{-3}$ and $\tau_{\text {min }}=$ $10^{-8} \mathrm{~s}$, which is illuminated in such a way that $g_{L}(t)$ hole-electron pairs $/ \mathrm{cm}^{2} \cdot \mathrm{~s}$ are generated uniformly throughout it. The waveform of $g_{L}(t)$ is periodic and is illustrated in Fig. P3.12.
(a) Show that $g_{L}(t)$ can be written as

$$
g_{L}(t)=G+g_{l}^{\prime}(t)
$$

where $G$ is the average value of $g_{L}(t)$ and $g_{l}^{\prime}(t)$ has zero average value, by sketching $G$ and $g_{l}(t)$. [Note that $g_{l}^{\prime}(t)$ becomes negative, which is not possible physically but is perfectly fine mathematically.]
(b) What is the average value of excess hole concentration $p^{\prime}$ in this sample?


FIGURE P3.12
(c) Sketch the solution for $p^{\prime}(t)$ corresponding to the excitation $g_{l}(t)$ you found in a, assuming $\tau_{\min } \gg 1 \mathrm{~ns}$.
(d) Your solution in (c) should look a lot like the integral of $g_{l}(t)$.
(i) Explain why this is the case.
(ii) Explain why a similar integration approach can't be used on $g_{L}(t)$ directly.
3.13 You are asked to design a light detector like that illustrated Fig. P3.13, in which the photoconductivity of a thin semiconductor film is used to sense the light. You are to choose the semiconductor from the choices listed below, select its carrier type and doping level, and specify the lateral dimensions of the device. Your design objective is to produce a detector that
(i) Has a conductance $G$ in the dark $\left(g_{L}=0\right)$ of under $10^{-4}$ mho
(ii) Displays a change in conductivity that is linearly proportional (within 10 percent) to the incident light intensity for $g_{L}$ up to $10^{20} \mathrm{~cm}^{-3} . \mathrm{s}$
(iii) Has à high sensitivity, defined as $d G / d g_{L}$, in its linear region
(iv) Has a high ratio of photocurrent to dark current

No lateral dimension in your device should be less than 2 microns or greater than 100 microns. The film is one micron thick, and the light generates carriers uniformly throughout it.

Choose the semiconductor from the following list. It can be either $n$ - or $p$-type and can have any doping level you want. The intrinsic carrier concentration at room temperature in both materials is less than $10^{10} \mathrm{~cm}^{-3}$.


FIGURE P3.13
(i) Semiconductor \#1: $\mu_{e}=2000 \mathrm{~cm}^{2} / V \cdot \mathrm{~s} ; \mu_{h}=0.1 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s} ; \tau_{\min }=10^{-4} \mathrm{~s}$
(ii) Semiconductor \#2: $\mu_{e}=3500 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s} ; \mu_{h}=500 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s} ; \tau_{\min }=10^{-4} \mathrm{~s}$

List the following items together on your solution in a clear manner:
(i) Which semiconductor you chose, its carrier type, and the doping level
(ii) Length $L$ and width $W$ of the device
(iii) Dark conductivity $G_{0}$
(iv) Sensitivitiy in the linear region and the bound on $g_{L}$ for this region
(v) Ratio of the photocurrent to the dark current

## NONUNIFORM SITUATIONS: THE FIVE BASIC EQUATIONS

We have looked at the carrier concentrations in a uniformly doped semiconductor in thermal equilibrium and also when uniformly excited by light. We have also looked at charge carrier motion under the influence of a uniform electric field (i.e., drift). Now we will consider nonuniform situations. We will consider both nonuniformly doped semiconductors, and uniformly doped semiconductors that are excited nonuniformly, for example, by light or at a contact or junction in a device. We want to learn how to find the carrier distributions, the electric fields, and the currents that in general will exist in such cases. The solutions to these types of problems play a central role in our models for diodes and bipolar transistors, as we shall see in Chaps. 7 and 8. We begin our treatment of nonuniform conditions by discussing diffusion and diffusion currents. We then discuss the formulation of five basic equations describing nonuniform situations in semiconductors.

### 4.1 DIFFUSION

We have already discussed the drift motion of charged particles under the influence of gradient in electrostatic potential (i.e., an electric field). Another "force" that can lead to a net movement of particles is a gradient in their concentration. This type of movement is called diffusion. Diffusion is a very widespread phenomenon that is encountered in many situations and has been applied in many useful ways. One important thing to realize about diffusion is that diffusing particles need not be electrically charged, as they must be in order to drift. Diffusion has nothing to
do with the electrical charge of the particles. If the particles do carry charge, however, then a diffusing flux of those particles will carry an electrical charge flux, or current. We will see this in detail later. For now we simply consider uncharged particles and look at the general process of diffusion.

### 4.1.1 A Model for Diffusion

Diffusion is the net motion of carriers in a concentration gradient. This motion results from the continual random thermal motion of the carriers. To see how this occurs and how we can express it mathematically, imagine that we have a concentration of particles of species $m, C_{m}$, that varies with position in the $x$-direction; that is, $C_{m}(x)$. These particles are at a finite temperature $T$ and have random thermal motion. We assume that the motion of any one particle is independent of the other particles and thus that the motion of the particles is random and independent of their concentration.

Now consider mentally dividing the sample into slabs, normal to the $x$ direction, that are $\Delta x$ thick. The slab centered about $x=x_{1}$ will contain approximately $\Delta x C_{m}\left(x_{1}\right)$ particles per unit area in the slab; per unit time a fraction $a$ of those particles will move (due to their random thermal motion) over to the slab at $x=x_{1}+\Delta x$, yielding a flow of particles to the right equal to $a(\Delta x) C_{m}\left(x_{1}\right)$ per unit area. This concept is illustrated in Fig. 4.1. Similarly, the slab centered at $x=x_{1}+\Delta x$ contains $\Delta x C_{m}\left(x_{1}+\Delta x\right)$ particles per unit area, the same fraction $a$ of which will move per unit time over to the slab at $x=x_{1}$. (The fractions $a$ are the same because we are assuming random, independent motion.) The net flow to the right across the plane between $x=x_{1}$ and $x=x_{1}+\Delta x$ is the difference of these two terms. This net flux density is

$$
\begin{equation*}
F_{m}=a \Delta x\left[C_{m}\left(x_{1}\right)-C_{m}\left(x_{1}+\Delta x\right)\right] \tag{4.1}
\end{equation*}
$$

We next use a Taylor's series expansion to relate $C_{m}\left(x_{1}\right)$ and $C_{m}\left(x_{1}+\Delta x\right)$ to the gradient of $C_{m}(x)$ at $x=x_{1}$

$$
\begin{equation*}
C_{m}\left(x_{1}+\Delta x\right) \approx C_{m}\left(x_{1}\right)+\left.\Delta x \frac{\partial C_{m}}{\partial x}\right|_{x=x_{1}} \tag{4.2}
\end{equation*}
$$



FIGURE 4.1
Illustration of the setup of the diffusion model of Sec. 4.1.1.

Using this expression in Eq. (4.1) yields

$$
\begin{equation*}
F_{m}=-a(\Delta x)^{2} \frac{\partial C_{m}}{\partial x} \tag{4.3a}
\end{equation*}
$$

Thus we find that a net flux exists because of the gradient in the concentration and is proportional to it; we call this flux the diffusion flux. We define the product $a(\Delta x)^{2}$ to be the diffusion coefficient $D_{m}$ of the species $m$ and write Eq. (4.3a) as

$$
\begin{equation*}
F_{m}=-D_{m} \frac{\partial C_{m}}{\partial x} \tag{4.3b}
\end{equation*}
$$

The diffusion coefficient $D_{m}$ has the units $\mathrm{cm}^{2} / \mathrm{s}$. The units of flux are particles/ $\mathrm{cm}^{2} \cdot \mathrm{~s}$, or simply $\mathrm{cm}^{-2} \cdot \mathrm{~s}^{-1}$. Equation (4.3) is the general diffusion relation; it is often called Fick's First Law.

In this model $D_{m}$ appears to depend on $\Delta x$, but one must remember that $a$ will also depend on $\Delta x$. The net result is that $D_{m}$ does not depend on $\Delta x$; that is, it is independent of the details of the model, as we know it must be. $D_{m}$ does, however, depend on temperature (exponentially, in fact), on the type of particles diffusing, and on the environment in which the particles are diffusing.

### 4.1.2 Diffusion Current Density

If the diffusing particles are charged we have a net charge flux, or current density, given by

$$
\begin{equation*}
J_{m}=q_{m} F_{m} \tag{4.4}
\end{equation*}
$$

where $q_{m}$ represents the charge on each particle. Focusing our discussion on holes and electrons in a semiconductor, we have the following:

$$
\begin{align*}
& \text { Hole diffusion current: } J_{h}^{\text {diff }}=-q D_{h} \frac{\partial p}{\partial x}  \tag{4.5a}\\
& \text { Electron diffusion current: } \quad J_{e}^{\text {diff }}=q D_{e} \frac{\partial n}{\partial x} \tag{4.5b}
\end{align*}
$$

Notice that for electrons we had to use $q_{m}=-q$, so the original minus sign has disappeared.

### 4.1.3 Other Diffusion Important in Devices

Diffusion is a very common phenomenon that has important applications in the fabrication of semiconductor devices as well as in their operation. One important means of introducing $n$ - and $p$-type dopants into a semiconductor is through diffusion. A high concentration of the dopant is established on the outside surface of the semiconductor, and it is allowed to diffuse into the surface. Negligible
dopant diffusion occurs at room temperature, but when silicon is heated to $1000^{\circ} \mathrm{C}$, for example, a dopant like boron will diffuse several microns into the surface in an hour or two. (See App. G for more discussion of this.)

### 4.2 MODELING NONUNIFORM SITUATIONS

With nonuniform excitation or doping, we anticipate that the excess carrier populations will be nonuniform, and since there will be gradients in the charge carrier concentrations, there will be diffusion currents. Furthermore, since the carriers will in general diffuse at different rates, we can anticipate that there will be charge imbalances from which an electric field will arise. An electric field implies that there will be drift currents as well as diffusion currents. All told, we will have a total of five unknown quantities to determine: the excess electron and hole concentrations, $n^{\prime}(x, t)$ and $p^{\prime}(x, t)$; the electron and hole currents, $J_{\mathrm{ex}}(x, t)$ and $J_{\mathrm{hx}}(x, t)$; and the electric field, $\mathscr{E}_{x}(x, t)$. As this notation indicates, these quantities will in general all be functions of position and time. Also, recall that we are restricting ourselves to variations in the $x$-direction only.

### 4.2.1 Total Current Densities

We have discussed drift currents and diffusion currents. In any general situation, the total electron and hole current densities are the sum of the respective drift and diffusion current densities:

$$
J_{h}=J_{h}^{\text {drift }}+J_{h}^{\text {diff }}
$$

and

$$
J_{e}=J_{e}^{\text {dift }}+J_{e}^{\text {diff }}
$$

Using Eqs. (3.8), (3.10), and (4.5), we can write

$$
\begin{equation*}
J_{h}=q p \mu_{h} \mathscr{E}_{x}-q D_{h} \frac{\partial p}{\partial x} \tag{4.6}
\end{equation*}
$$

and

$$
\begin{equation*}
J_{e}=q n \mu_{e} \mathscr{E}_{x}+q D_{e} \frac{\partial n}{\partial x} \tag{4.7}
\end{equation*}
$$

The total current density is, of course, the sum of the electron and hole current densities:

$$
\begin{equation*}
J_{\mathrm{tot}}=J_{h}+J_{e} \tag{4.8}
\end{equation*}
$$

These expressions for the electron and hole currents give us two of the equations we need relating to our five unknowns.

### 4.2.2 The Continuity Equations

When we discussed generation and recombination in uniformly excited uniformly doped material, we had the following equations relating the hole or electron concentration at a point to the net generation or recombination occurring at that point:

$$
\begin{equation*}
\frac{d n}{d t}=\frac{d p}{d t}=g_{L}-r\left(n p-n_{o} p_{0}\right) \tag{3.23'}
\end{equation*}
$$

In nonuniformly excited or doped material we must modify these equations to account for the fact that there is now another mechanism by which the carrier concentrations can change; namely, through nonuniform flow of particles. Before proceeding to do this, however, it is also worth noting that the product $n_{o} p_{0}$ is still $n_{i}^{2}$, even if $n_{o}$ and $p_{o}$ are functions of position, and $n_{i}^{2}$ is, of course, not a function of position.

Consider a given region in a sample. If the particle flux into that region is the same as the flux out, there will be no net increase or decrease in the particle concentration in that region. If, however, the flux out is larger than the flux in, the concentration must be decreasing with time. If the flux out is smaller, then the opposite is true. We can state this mathematically (in one dimension) as

$$
\begin{equation*}
\frac{\partial C_{m}}{\partial t}=\frac{-\partial F_{m}}{\partial x} \tag{4.9}
\end{equation*}
$$

where $C_{m}$ is the particle concentration and $F_{m}$ is the flux $\left(\mathrm{cm}^{-2}-\mathrm{s}^{-1}\right)$. This expression is another basic diffusion equation known as Fick's Second Law. To see where this result comes from, consider a region located between $\dot{x}=x_{1}$ and $x=x_{1}+\Delta x$ that is $\Delta x$ long in the $x$-direction and has a cross-sectional area (normal to $x$ ) of $A$. For simplicity we will consider only a one-dimensional problem, so we restrict the flux to the $x$-direction and allow it to vary only with $x$; that is, we have $F_{m}(x)$. The number of particles entering the region from the left per unit time is $A F_{m}(x)$, and the number leaving to the right at $x=x_{1}+\Delta x$ is $A F_{m}\left(x_{1}+\Delta x\right)$. The rate of increase in the number of particles $M$ in the region is given by

$$
\begin{equation*}
\frac{\partial M}{\partial t}=A\left[F_{m}\left(x_{1}\right)-F_{m}\left(x_{1}+\Delta x\right)\right] \tag{4.10}
\end{equation*}
$$

Expanding about $x_{1}$ we obtain

$$
F_{m}\left(x_{1}+\Delta x\right) \approx F_{m}\left(x_{1}\right)+\frac{\partial F_{m}\left(x_{1}\right)}{\partial x} \Delta x
$$

which, when substituted into Eq. (4.10), gives us

$$
\begin{equation*}
\frac{\partial M}{\partial t}=-A \Delta x \frac{\partial F_{m}}{\partial x} \tag{4.11}
\end{equation*}
$$

Dividing by the volume of the region to get the particle density, we have

$$
\begin{equation*}
\frac{\partial C_{m}}{\partial t}=-\frac{\partial F_{m}}{\partial x} \tag{4.12}
\end{equation*}
$$

Returning now to our original problem, we want to generalize Eq. (3.23) to nonuniform situations by adding the change in the carrier concentration due to the gradient in the particle fluxes or, in this case, currents. We divide the currents by the charge on the carriers and add these components to the previous equations:

$$
\begin{equation*}
\frac{\partial n}{\partial t}=g_{L}-r\left(n p-n_{i}^{2}\right)-\frac{1}{-q} \frac{\partial J_{e}}{\partial x} \tag{4.13a}
\end{equation*}
$$

and

$$
\begin{equation*}
\frac{\partial p}{\partial t}=g_{L}-r\left(n p-n_{i}^{2}\right)-\frac{1}{+q} \frac{\partial J_{h}}{\partial x} \tag{4.13b}
\end{equation*}
$$

Note that we write the derivatives as partials because now $n, p$, and $J$ can all be functions of both $x$ and $t$. We have also replaced $n_{o} p_{o}$ with $n_{i}^{2}$.

Note that the $g_{L}$ and $r\left(n p-n_{i}{ }^{2}\right)$ terms are common to both equations, so we often write these equations as

$$
\begin{equation*}
\frac{\partial n}{\partial t}-\frac{1}{q} \frac{\partial J_{e}}{\partial x}=\frac{\partial p}{\partial t}+\frac{1}{q} \frac{\partial J_{h}}{\partial x}=g_{L}-r\left(n p-n_{i}^{2}\right) \tag{4.13c}
\end{equation*}
$$

These continuity equations, as they are termed, give us two additional relationships between the carrier concentrations and fluxes, bringing our total number of equations to four.

### 4.2.3 Gauss's Law

The fifth equation we need to begin solving for our five unknowns is Gauss's law, which relates the net charge at any point to the gradient in the electric field. In one dimension this is

$$
\begin{equation*}
\frac{\partial[\varepsilon(x) \mathscr{E}(x, t)]}{\partial x}=\rho(x, t) \tag{4.14}
\end{equation*}
$$

where $\varepsilon(x)$ is the dielectric constant. Writing out $\rho(x, t)$ we have

$$
\frac{\partial[\varepsilon(x) \mathscr{E}(x, t)]}{\partial x}=q\left[p(x, t)-n(x, t)+N_{d}(x)-N_{a}(x)\right]
$$

This is the final relationship we need relating our five unknowns.

### 4.2.4 The Five Basic Equations

We collect the five equations together below:

$$
\begin{equation*}
J_{e}(x, t)=q n(x, t) \mu_{e}(x) \mathscr{E}(x, t)+q D_{e}(x) \frac{\partial n(x, t)}{\partial x} \tag{4.15}
\end{equation*}
$$

$$
\begin{align*}
J_{h}(x, t) & =q p(x, t) \mu_{h}(x) \mathscr{E}(x, t)-q D_{h}(x) \frac{\partial p(x, t)}{\partial x}  \tag{4.16}\\
-\frac{1}{q} \frac{\partial J_{e}(x, t)}{\partial x}+\frac{\partial n(x, t)}{\partial t} & =g_{L}(x, t)-r(T)\left[p(x, t) n(x, t)-n_{i}^{2}(T)\right]  \tag{4.17}\\
\frac{1}{q} \frac{\partial J_{h}(x, t)}{\partial x}+\frac{\partial p(x, t)}{\partial t} & =g_{L}(x, t)-r(T)\left[p(x, t) n(x, t)-n_{i}^{2}(T)\right]  \tag{4.18}\\
\frac{\partial[\varepsilon(x) \mathscr{E}(x, t)]}{\partial x} & =q\left[p(x, t)-n(x, t)+N_{d}(x)-N_{a}(x)\right] \tag{4.19}
\end{align*}
$$

This set of equations forms the starting point for our analysis of semiconductor devices. These differential equations are, however, coupled and nonlinear and are in general very difficult to solve, even with the aid of a large computer. Fortunately there is a broad class of problems, flow problems, that form an important subset in which significant simplifications can be made and the five equations can be linearized and largely decoupled. We address this subset in the next chapter. There is yet another broad class of problems, $p-n$ junctions, for which a second set of approximations and simplifications can be made, leading again to analytical models. We will discuss these problems in Chap. 6.

### 4.3 SUMMARY

In this chapter, we began our consideration of nonuniform situations and introduced the very important concept of diffusion, the second mechanism-along with drift-by which charge carriers move, and thus current flows, in semiconductors. We saw, however, that diffusion does not depend on charge or electric fields; it occurs simply because a concentration gradient exists. Nonetheless, if the diffusing particles are charged, their diffusion leads to a diffusion current density.

Having defined diffusion, we then looked at defining the scope of the problem we face under nonuniform situations and at the equations at our disposal to model them. We identified five "unknowns": the two carrier concentrations, the two corresponding carrier fluxes (currents), and the electric field; and we developed five equations, collected above as Eqs. (4.15) through (4.19), which can be solved for the five unknowns. Their solutions in two special sets of circumstances will be the topics of Chaps. 5 and 6.

## PROBLEMS

4.1 (a) The diffusion coefficient for boron in silicon is $2 \times 10^{-14} \mathrm{~cm}^{2} / \mathrm{s}$ at $1000^{\circ} \mathrm{C}$. Use this fact and the definition of $D$ in terms of $a$ and $\Delta x$ that precedes Eq. (4.3b) to estimate the rate at which boron atoms move from lattice site to lattice site ( $\Delta x \approx 2.5 \AA$ ) in Si at $1000^{\circ} \mathrm{C}$.
(b) As a function of temperature, the diffusion coefficient of silicon can be written as $D_{o} e^{-E_{a} / k T}$ where $D_{o}$ is $2 \mathrm{~cm}^{2} / \mathrm{s}, E_{a}$ is 3.5 eV and $k$ is $8.62 \times 10^{-5} \mathrm{eV} / \mathrm{K}$. Using this information, verify the value for $D$ given in Part (a).
(c) Calculate the diffusion coefficient of boron in Si at room temperature, and again estimate the rate at which boron atoms move to a new lattice site.
(d) Repeat Part (c) at $1150^{\circ} \mathrm{C}$.
4.2 Simplify the five equations in the special case of uniform material under uniform time-varying low-level optical excitation, and show that they reduce to Eqs. (3.33) and (3.34).
4.3 Simplify the five equations in the special case of uniform material with no optical excitation and with a uniform, constant electric field within the sample, and show that they reduce to Eq. (3.12).
4.4 Basic models for solid-state diffusion, that is, the diffusion of dopant atoms in a semiconductor, assume that the diffusing atoms are uncharged and that there is thus no drift component to their flux. The only flux is that due to diffusion and is given by Fick's First Law, Eq. (4.3). Furthermore, there is no generation or recombination of atoms, so the only way the concentration of atoms at a point can change with time is if there is a divergence in the flux, as shown by Fick's Second Law, Eq. (4.9). These two equations give us the two relationships we need between the two unknowns in this problem, the concentration $C_{m}(x, t)$ and flux $F_{m}(x, t)$.
(a) Combine Eqs. (4.3b) and (4.9) to get a differential equation for $C_{m}(x, t)$.
(b) Show that the expression

$$
C_{m}^{\prime}(x, t)=\frac{A}{\sqrt{\pi D_{m} t}} \exp \left[\frac{-\left(x-x_{o}\right)^{2}}{4 D_{m} t}\right]
$$

satisfies the equation you found in (a). A curve with this shape is called a Gaussian.
(c) When a fixed number of dopant atoms is introduced in a shallow layer on a semiconductor surface and they diffuse into the surface over time, their profile is Gaussian (see App. G, Fig. G.3b).
(i) Show that a Gaussian fits the boundary constraints of this type of a problem by showing that

$$
\int_{-\infty}^{\infty} C_{m}(x, t) d x=\text { Constant independent of } t
$$

and

$$
\lim _{t \rightarrow 0} C_{m}(x, t)=\left\{\begin{array}{c}
0 \text { if } x \neq x_{0} \\
\infty \text { if } x=x_{0}
\end{array}\right\}
$$

(ii) Explain the significance of each of these relationships.
(d) If a Gaussian satisfies the differential equation you found in (a), so too will an infinite sum of Gaussians. An important sum is the error function erf(y), defined as

$$
\operatorname{erf}(y) \equiv \frac{2}{\sqrt{\pi}} \int_{0}^{y} e^{-\alpha^{2}} d \alpha
$$

and another is the complementary error function erfc ( $y$ ), defined as

$$
\operatorname{erfc}(y) \equiv 1-\operatorname{erf}(y)
$$

Look up the properties of the complementary error function in a mathematics reference, and show that it fits the boundary conditions of diffusion into a semi-
conductor surface in which the concentration at the surface is held fixed, that is, $C_{m}(0, t)=$ constant. (See App. G, Fig. G.3a.)
4.5 Our equations for current density, Eqs. (4.15) and (4.16), can be viewed as composed of a diffusion current density due to a gradient in the concentration and a drift current density due to a gradient in the electrostatic potential (because $\mathscr{E}=-\partial \phi / \partial x$ ). If we remove our requirement of constant temperature, we must add another term to the current density, namely, one due to a gradient in the temperature.
(a) Add electron and hole flux current density terms to Eqs. (4.15) and (4.16) that are proportional to the gradient in the temperature, $\partial / \partial T$.
(b) What are the signs on the terms you added in (a)? Explain your reasoning.
(c) How do the terms you added depend on the carrier concentrations? Rewrite them, if necessary, to show this dependence explicitly.

## CHAPTER

 5
## NONUNIFORM CARRIER INJECTION: FLOW PROBLEMS

An important set of problems for which we can get analytical solutions to the five basic equations developed in Chap. 4 [Eqs. (4.15) through (4.19)] are those involving nonuniform, low-level, essentially static injection of carriers into a uniform extrinsic semiconductor. Although you have no reason a priori to suspect that such problems are of interest to anybody, these problems, which we will call flow problems, are at the heart of $p-n$ diode and bipolar transistor operation. Understanding flow problems is essential to our modeling of these devices, and developing that understanding is our goal in this chapter.

### 5.1 DEVELOPING THE DIFFUSION EQUATION

To proceed with a solution of the five basic equations relating the carrier populations, currents, and electric field, we restrict ourselves to situations in which the following five assumptions are valid:

1. The material is extrinsic and uniformly doped.
2. There is only low-level injection.
3. There is very little net charge density; that is, the material is quasineutral.
4. The minority carrier drift current is negligible.
5. There is very little variation with time; that is, the excitation is quasistatic.

We will look in turn at each of these assumptions before arriving at our ultimate goal, the diffusion equation.

### 5.1.1 Uniformly Doped Extrinsic Material

If the material we are considering is extrinsic and is uniformly doped, then we know the equilibrium electron and hole concentrations, $n_{0}$ and $p_{0}$, already and just have to find the excess electron and hole populations, $n^{\prime}(x, t)$ and $p^{\prime}(x, t)$, respectively. Furthermore, any spatial or temporal derivatives of the populations, $n(x, t)$ and $p(x, t)$, reduce to derivatives of the excess populations, $n^{\prime}(x, t)$ and $p^{\prime}(x, t)$, because the equilibrium concentrations are functions of neither time nor position. Thus we have

$$
\frac{\partial n}{\partial x}=\frac{\partial n^{\prime}}{\partial x}, \quad \frac{\partial p}{\partial x}=\frac{\partial p^{\prime}}{\partial x}
$$

and

$$
\begin{equation*}
\frac{\partial n}{\partial t}=\frac{\partial n^{\prime}}{\partial t}, \quad \frac{\partial p}{\partial t}=\frac{\partial p^{\prime}}{\partial t} \tag{5.1}
\end{equation*}
$$

Finally, we know that $N_{d}(x)-N_{a}(x)$ can be related to $p_{0}-n_{0}$ as

$$
\begin{equation*}
p_{o}-n_{o}+N_{d}(x)-N_{a}(x)=0 \tag{5.2}
\end{equation*}
$$

so that the last of our five basic equations, Eq. (4.19), reduces to

$$
\begin{equation*}
\varepsilon \frac{\partial \mathscr{C}(x, t)}{\partial x}=q\left[p^{\prime}(x, t)-n^{\prime}(x, t)\right] \tag{5.3}
\end{equation*}
$$

Notice that in writing Eq. (5.3) we have used the fact that our material is uniform to conclude that the dielectric constant $\varepsilon$ is not a function of $x$, so it can be pulled out of the derivative.

### 5.1.2 Low-Level Injection

Recall that by low-level injection we mean that the excess carrier concentrations must be much less than the majority carrier concentration. A general way of writing the low-level injection condition is

$$
\begin{equation*}
n^{\prime}, p^{\prime} \ll p_{0}+n_{0} \tag{5.4}
\end{equation*}
$$

The sum on the right is essentially just the majority carrier concentration because in extrinsic material the equilibrium population of majority carriers is many orders of magnitude larger than the minority carrier population.

If low-level injection conditions exist, we can remove the nonlinearity in the continuity equations, Eqs. (4.17) and (4.18), as we have seen in Chap. 3. To review, we begin with

$$
\begin{equation*}
G-R=G_{o}+g_{L}(x, t)-n p r \tag{5.5a}
\end{equation*}
$$

Replacing $G_{o}$ with $n_{o} p_{o} r$ yields

$$
\begin{equation*}
G-R=g_{L}(x, t)-\left(n p-n_{o} p_{o}\right) r \tag{5.5b}
\end{equation*}
$$

Next, replacing $n$ and $p$ with $\left(n_{o}+n^{\prime}\right)$ and $\left(p_{o}+p^{\prime}\right)$, respectively, neglecting the term involving the product $n^{\prime} p^{\prime}$, and assuming $n^{\prime} \simeq p^{\prime}$ (which we will justify in the following subsection) we have

$$
\begin{equation*}
G-R \approx g_{L}(x, t)-n^{t}\left(n_{0}+p_{0}\right) r \tag{5.5c}
\end{equation*}
$$

We may write

$$
\begin{equation*}
G-R \approx g_{L}(x, t)-\frac{n^{\prime}}{\tau_{\min }} \tag{5.5d}
\end{equation*}
$$

if we define the minority carrier lifetime $\tau_{\min }$ as

$$
\begin{equation*}
\tau_{\min } \equiv \frac{1}{\left(n_{o}+p_{o}\right) r} \tag{5.6}
\end{equation*}
$$

Thus, under low-level injection conditions, Eqs. (4.17) and (4.18) become

$$
\begin{equation*}
\frac{\partial n^{\prime}}{\partial t}-\frac{1}{q} \frac{\partial J_{e}}{\partial x}=g_{L}(x, t)-\frac{n^{\prime}}{\tau_{\min }} \tag{5.7a}
\end{equation*}
$$

and

$$
\begin{equation*}
\frac{\partial p^{\prime}}{\partial t}+\frac{1}{q} \frac{\partial J_{h}}{\partial x}=g_{L}(x, t)-\frac{n^{\prime}}{\tau_{\min }} \tag{5.7~b}
\end{equation*}
$$

When we are dealing with extrinsic material, as we are here, either $p_{o}$ or $n_{o}$ will dominate the sum $p_{o}+n_{o}$ in the definition of the minority carrier lifetime, so it is more common to write Eq. (5.6) as

$$
\tau_{\min } \equiv \tau_{e} \approx \frac{1}{p_{o} r}
$$

in p-type material, and as

$$
\tau_{\min } \equiv \tau_{h} \approx \frac{1}{n_{o} r}
$$

in $n$-type material.

### 5.1.3 Quasineutrality

By quasineutrality we mean that any charge imbalances are small, that is, that

$$
\begin{equation*}
n^{\prime}(x, t) \approx p^{\prime}(x, t) \tag{5.8}
\end{equation*}
$$

and

$$
\begin{equation*}
\frac{\partial n^{\prime}(x, t)}{\partial x} \approx \frac{\partial p^{\prime}(x, t)}{\partial x} \tag{5.9}
\end{equation*}
$$

We don't mean that these quantities are equal; rather, their differences are much smaller than their sums:

$$
\begin{equation*}
\left|n^{\prime}-p^{\prime}\right| \ll n^{\prime}+p^{\prime} \tag{5.10}
\end{equation*}
$$

and

$$
\begin{equation*}
\left|\frac{\partial n^{\prime}}{\partial x}-\frac{\partial p^{\prime}}{\partial x}\right| \ll\left|\frac{\partial n^{\prime}}{\partial x}+\frac{\partial p^{\prime}}{\partial x}\right| \tag{5.11}
\end{equation*}
$$

Quasineutrality is a very important concept. It is also a very rugged assumption in most semiconductors because the mobile majority charge carriers readily move so as to reduce and essentially eliminate any deviations from neutrality. Simplistically, the negative and positive charge distributions attract each other and, if possible, move together to balance each other out.

We can quantify our argument that quasineutrality is a widely applicable assumption by examining the spatial and temporal characteristics of ( $p^{\prime}-n^{\prime}$ ). We find (see App. D) that temporal deviations from quasineutrality dissipate on a time scale on the order of the dielectric relaxation time $\tau_{D}$, given by

$$
\begin{equation*}
\tau_{D} \equiv \frac{\varepsilon}{\sigma_{o}} \tag{5.12}
\end{equation*}
$$

where $\varepsilon$ is the dielectric constant and $\sigma_{o}$ is the thermal equilibrium conductivity. We also find (again see App. D) that spatial deviations from quasineutrality dissipate within a few extrinsic Debye lengths, $L_{\text {De }}$, given by

$$
\begin{equation*}
L_{\mathrm{De}} \equiv \sqrt{D_{\mathrm{maj}} \tau_{D}} \tag{5.13}
\end{equation*}
$$

where $D_{\text {maj }}$ is the majority carrier diffusion coefficient.

## Example

Question. A moderately low conductivity semiconductor might have a conductivity $\sigma_{o}$, of $1 \mathrm{~S} / \mathrm{cm}$. What are the dielectric relaxation time and extrinsic Debye length in such a sample? Assume that the majority carrier diffusion constant $D_{\text {maj }}$ has a value typical of $n$-type silicon, $16 \mathrm{~cm}^{2} / \mathrm{s}$. The permittivity $\varepsilon$ of silicon is approximately $10^{-12} \mathrm{C} / \mathrm{V} \cdot \mathrm{cm}$.

Discussion. Using Eq. (5.12), we find that the dielectric relaxation time $\tau_{D}$ is one picosecond, (i.e., $10^{-12} \mathrm{~s}$ ). This result tells us that it is hard to maintain an appreciable difference between $p^{\prime}$ and $n^{\prime}$ for more than a few picoseconds in such a sample.

Next, using Eq. (5.13) and this value for the dielectric relaxation time, we calculate that the extrinsic Debye length $L_{\mathrm{De}}$, is $4 \times 10^{-6} \mathrm{~cm}$, or $400 \AA$. Again this result tells us that any deviations from charge neutrality will exist only over very short distances.

All told, the tendency to quasineutrality is very strong in a typical semiconductor. We have already used it to linearize the continuity equations in Sec. 5.1.2, and we will use it again in the next section.

It is important to note that we are not saying that $n^{\prime}$ equals $p^{\prime}$, for that would mean that there is no gradient in the electric field [see Eq. (5.3)]. We are saying, however, that $n^{\prime}$ and $p^{\prime}$ are similar, and in many cases one can be substituted for the other. On the other hand, when the difference between $n^{\prime}$ and $p^{\prime}$ is important, as in Eq. (5.3), we must be more careful.

### 5.1.4 Minority Carriers Flow by Diffusion

A traditional assumption is given by the statement "Minority carriers flow only by diffusion." What this really means is that under low-level injection conditions the minority carrier drift current is always a very small fraction of the total current. Thus if we have to worry about the minority carrier current at all in flow problems, the minority carrier diffusion current will be what matters.

The conclusion that minority carrier drift current is unimportant in extrinsic material should not be surprising to you because you already know that the majority carrier population is significantly greater than the minority carrier population as long as low-level injection conditions hold. Thus the minority drift current will be much, much less than the majority carrier drift current.

The minority and majority carrier diffusion currents, on the other hand, depend not on the total number of carriers but rather on their gradients; and their gradients are comparable [Eq. (5.9)]. The diffusion coefficients for holes and electrons, $D_{h}$ and $D_{e}$, are also of the same order of magnitude, so the diffusion currents of holes and electrons tend to be of comparable magnitude (but, of course, of opposite sign).

We can make no general statement with respect to the relative sizes of the majority carrier drift current and the two diffusion currents other than to say that there are no restrictions. Sometimes the current is essentially all majority carrier drift, other times it is all majority and minority carrier diffusion; still other times it comprises comparable magnitudes of majority carrier drift and diffusion and minority carrier diffusion components.

However, we can in general say that it is probably correct to assume that the minority carrier drift current is negligibly small in flow problems. We can say this because we realize that the minority carrier diffusion current is the only component of the minority carrier current that has a chance of being comparable to, or larger than, the majority carrier drift current. Thus, if there is any appreciable minority carrier current, it must be the minority carrier diffusion current and we can therefore approximate the total minority carrier current density as simply

$$
\begin{equation*}
J_{\min }=-q_{\min } D_{\min } \frac{\partial C_{\min }}{\partial x} \tag{5.14}
\end{equation*}
$$

This single observation has an enormous simplifying impact on our set of equations. It removes the nonlinear product term of the minority carrier concentration and the electric field from the equation for the minority carrier current, and in fact eliminates the electric field from that equation altogether.

### 5.1.5 Time-Dependent Diffusion Equation

Before considering the fifth assumption-that our excitation is quasistatic-we should rewrite our five equations in light of our assumptions thus far. Since we know that it matters which are the minority and majority carriers, let us assume for the sake of discussion that we are considering a $p$-type sample. We then use our assumptions to write

$$
\begin{gather*}
J_{e}(x, t) \approx q D_{e} \frac{\partial n^{\prime}(x, t)}{\partial x}  \tag{5.15}\\
J_{h}(x, t) \approx q \mu_{h} p_{o} \mathscr{E}(x, t)-q D_{h} \frac{\partial p^{\prime}(x, t)}{\partial x}  \tag{5.16}\\
-\frac{1}{q} \frac{\partial J_{e}(x, t)}{\partial x}+\frac{\partial n^{\prime}(x, t)}{\partial t}+\frac{n^{\prime}(x, t)}{\tau_{e}}=g_{L}(x, t)  \tag{5.17}\\
\frac{1}{q} \frac{\partial J_{h}(x, t)}{\partial x}+\frac{\partial p^{\prime}(x, t)}{\partial t}+\frac{n^{\prime}(x, t)}{\tau_{e}}=g_{L}(x, t)  \tag{5.18}\\
\varepsilon \frac{\partial \mathscr{E}(x, t)}{\partial x}=q\left[p^{\prime}(x, t)-n^{\prime}(x, t)\right] \tag{5.19}
\end{gather*}
$$

Our set of five equations is now completely linear, and some of the coupling has been eliminated. In fact, we see that Eqs. (5.15) and (5.17) now each involve only the excess minority carrier concentration $n^{\prime}(x, t)$ and the minority carrier current $J_{e}(x, t)$; they form a set of two equations in two unknowns. Eliminating $J_{e}(x, t)$ from them by inserting Eq. (5.15) into Eq. (5.17) results in a single linear differential equation for $n^{\prime}(x, t)$ :

$$
\begin{equation*}
\frac{\partial n^{\prime}(x, t)}{\partial t}-D_{e} \frac{\partial^{2} n^{\prime}(x, t)}{\partial x^{2}}+\frac{n^{\prime}(x, t)}{\tau_{e}}=g_{L}(x, t) \tag{5.20}
\end{equation*}
$$

This equation describes the diffusion of minority carriers under low-level injection conditions in a uniformly doped, extrinsic semiconductor, but it turns out to be even more general than that. It describes the motion of any particles moving primarily only by diffusion. It describes, for example, the diffusion of dopant atoms into silicon.

We have already seen Eq. (5.20) in the special case of uniform excitation. In this situation there is no dependence on $x$, and the $\partial^{2} / \partial x^{2}$ term is zero. In this case, Eq. (5.20) reduces to Eq. (3.32).

We will not at this point consider solutions to Eq. (5.20) when we have both space and time variations. Rather, we next restrict ourselves to situations where the time variations are negligible.

### 5.1.6 Quasistatic Diffusion: Flow Problems

If the variation of $g_{L}(x, t)$ with time is slow enough that the time derivatives of the carrier concentrations are small relative to the other terms in the equation, we say we have a quasistatic excitation and that we can make the quasistatic approx-
imation. For convenience, we will tend to concentrate on problems where there is no time variation of $g_{L}$, but this is, strictly speaking, unnecessarily restrictive. We can have time variation if all of the time derivatives are negligibly small and things look essentially static (i.e., quasistatic).

With the quasistatic approximation, our equation for $n^{\prime}$ (Eq. 5.20) becomes, after dividing by $-D_{e}$,

$$
\begin{equation*}
\frac{d^{2} n^{\prime}}{d x^{2}}-\frac{n^{\prime}}{D_{e} \tau_{e}}=-\frac{g_{L}(x)}{D_{e}} \tag{5.21a}
\end{equation*}
$$

Note that the derivative is now a total, rather than a partial, derivative. The quantity $D_{e} \tau_{e}$ has units of length squared, so we may write

$$
\begin{equation*}
\frac{d^{2} n^{\prime}}{d x^{2}}-\frac{n^{\prime}}{L_{e}^{2}}=-\frac{g_{L}(x)}{D_{e}} \tag{5.21b}
\end{equation*}
$$

where $L_{e}$, a minority carrier diffusion length, is given by

$$
\begin{equation*}
L_{e} \equiv \sqrt{D_{e} \tau_{e}} \tag{5.22}
\end{equation*}
$$

Equation ( 5.21 b ) is a second-order linear differential equation that we will call the quasistatic diffusion equation. We will discuss solving it for the minority carrier concentration in the next section. Before doing that, however, we want to show that once we have solved Eq. (5.21b), we can solve for our other unknowns in short order.

Once we know the minority carrier concentration, in this case $n^{\prime}(x)$, and have verified our assumption of low-level injection, we can immediately get the minority carrier current density $J_{e}(x)$ using the quasistatic approximation to Eq. (5.15):

$$
\begin{equation*}
J_{e}(x)=q D_{e} \frac{d n^{\prime}}{d x} \tag{5.23}
\end{equation*}
$$

Assuming we know the total current density $J_{\mathrm{TOT}}$, we next calculate the majority carrier current density as

$$
\begin{equation*}
J_{h}(x)=J_{\mathrm{TOT}}-J_{e}(x) \tag{5.24}
\end{equation*}
$$

This may seem unreasonable because we have said nothing thus far about $J_{\text {TOT }}$, but the problem being solved will often be defined in such a way that the total current density $J_{\text {TOT }}$ is known at at least one point. This is sufficient to tell us $J_{\text {TOT }}$ at all $x$ because we can show that $J_{\text {TOT }}$ will not change with position if the excitation is quasistatic. To see that this is true, we first subtract Eq. (5.17) from Eq. (5.18) to yield

$$
\begin{equation*}
\frac{1}{q} \frac{d J_{h}(x)}{d x}+\frac{1}{q} \frac{d J_{e}(x)}{d x}=0 \tag{5.25a}
\end{equation*}
$$

which we can also write as

$$
\begin{equation*}
\frac{d}{d x}\left[J_{h}(x)+J_{e}(x)\right]=0 \tag{5.25b}
\end{equation*}
$$

Identifying $J_{\text {TOT }}$ as $J_{h}(x)+J_{e}(x)$ we have

$$
\begin{equation*}
\frac{d J_{\mathrm{TOT}}}{d x}=0 \tag{5.25c}
\end{equation*}
$$

This last result tells us that $J_{\text {TOT }}$ is not a function of position. Thus if we know $J_{\text {TOT }}$ anywhere (even at only one position $x$ ), we know it everywhere. Fortunately, as we will discuss at greater length in Section 5.2.4, we will in general be able to find $J_{\text {TOT }}$ in any given problem with little difficulty.

From $J_{h}(x)$ we calculate the electric field $\mathscr{E}(x)$ using Eq. (5.16) and quasineutrality (i.e., $d n^{\prime} / d x \approx d p^{\prime} / d x$ ). We have

$$
\begin{equation*}
\mathscr{E}(x) \approx \frac{J_{h}(x)+q D_{h}\left(d n^{\prime} / d x\right)}{q \mu_{h} p_{o}} \tag{5.26}
\end{equation*}
$$

Next, we calculate $p^{\prime}(x)$ using Eq. (5.19), which gives us

$$
\begin{equation*}
p^{\prime}(x)=n^{\prime}(x)+\frac{\varepsilon}{q}\left(\frac{d \mathscr{E}}{d x}\right) \tag{5.27}
\end{equation*}
$$

Finally, we compare our result for $p^{\prime}$ to our $n^{\prime}$ in order to verify our assumption of quasineutrality. As with any solution involving assumptions, our last step must be to check that all of our assumptions are valid.

Clearly, our first and most involved problem is to find the excess minority carrier population. After we have done that, everything else follows rather directly and readily. Thus we turn next to solving the quasistatic diffusion equation.

### 5.2 FLOW PROBLEMS

We will refer to problems involving the solution of Eq. (5.21b) under various boundary conditions and with various excitations $g_{L}(x)$ as flow problems. Developing an understanding of the solutions of flow problems is a very important step in understanding semiconductor devices.

### 5.2.1 Homogeneous Solutions

The homogeneous solution to Eq. (5.21b), that is, the $n^{\prime}(x)$ that satisfies this equation with the excitation $g_{L}(x)$ set to zero is

$$
\begin{equation*}
n^{\prime}(x)=A e^{x / L_{e}}+B e^{-x / L_{e}} \tag{5.28}
\end{equation*}
$$

where $A$ and $B$ are constants whose values we will determine later by requiring that the total solution, which is the sum of the homogeneous and particular solutions, satisfies the boundary conditions.

Equation (5.28) can also be written in terms of hyperbolic sine and cosine functions as

$$
\begin{equation*}
n^{\prime}(x)=C \cosh \left(\frac{x}{L_{e}}\right)+D \sinh \left(\frac{x}{L_{e}}\right) \tag{5.29}
\end{equation*}
$$

The two constants $C$ and $D$ are related to the constants $A$ and $B$ in Eq. (5.28) as $C=(A+B) / 2$ and $D=(A-B) / 2$.

Looking at either Eq. (5.28) or (5.29), we see that the minority carrier diffusion length $L_{e}$ is an index by which dimensions can be judged. That is, in any particular problem, saying that a length $w$ is "very small" would mean $w$ is small relative to $L_{e}$ (i.e., $w \ll L_{e}$ ); whereas saying that $w$ is "very large" would correspond to $w>L_{e}$. Conversely, saying that the minority carrier diffusion length is very long in a given sample implies that $L_{e} \gg w$, and saying it is short implies the opposite.

We will see later during our discussion of junction devices that it is often advantageous to make the dimensions of devices very small relative to the minority carrier diffusion length. In such situations, the parameter $x$ will also always be much less than the minority carrier diffusion length and we can then simplify the homogeneous solution by using the approximation

$$
\begin{equation*}
e^{ \pm x / L_{e}} \approx 1 \pm \frac{x}{L_{e}} \tag{5.30}
\end{equation*}
$$

when $x \ll L_{e}$. With this substitution, the homogeneous solution for $n^{\prime}(x)$, Eq. (5.28), can be approximated as

$$
\begin{equation*}
n^{\prime}(x) \approx(A+B)+(A-B) \frac{x}{L_{e}} \tag{5.31a}
\end{equation*}
$$

Thus we see that in the special case of a small device, or equivalently, a large minority carrier diffusion length $w \ll L_{e}$, the value of $n^{\prime}(x)$ varies approximately linearly with position:

$$
\begin{equation*}
n^{\prime}(x) \approx E x+F \tag{5.31b}
\end{equation*}
$$

where $E$ and $F$ are related to our earlier $A$ and $B$ as $E=(A-B) / L_{e}$ and $F=A+B$.

The minority carrier lifetime is a material parameter that is affected by the purity and crystalline quality as well as by the sample's processing history, whereas the diffusion coefficient (which plays an equal role in determining the minority carrier diffusion length) varies much less from sample to sample. Thus differences in the minority carrier lifetime are the primary reason that the minority carrier diffusion length might vary from sample to sample of a given material. We often speak of cases for which $w \ll L_{e}$ and for which $n^{\prime}(x)$ can be approximated by a linear equation [i.e., Eq. (5.31b)] as corresponding to an infinite lifetime. In this regard, it is a useful exercise to look at Eq. (5.21a) in the limit $\tau_{e} \rightarrow \infty$. In this limit Eq. (5.21a) becomes

$$
\begin{equation*}
\frac{d^{2} n^{\prime}}{d x^{2}} \approx \frac{-g_{L}(x)}{D_{e}} \tag{5.32}
\end{equation*}
$$

Clearly Eq. (5.31b) is the homogeneous solution to this second-order linear differential equation.

### 5.2.2 Particular Solutions

Determining the particular solution requires knowledge of the excitation function $g_{L}(x)$, and we will present several specific examples in Section 5.2.4. For now, we will simply make a general comment about obtaining a particular solution.

Often an excitation function $g_{L}(x)$ will have different functional forms in different sections of the sample. A simple, very common example involves having only a portion of the sample illuminated, that is, when $g_{L}(x)$ is nonzero only between $x=x_{1}$ and $x=x_{2}$ and is zero elsewhere. In such cases, it is advisable to divide the problem of finding particular and total solutions accordingly. Particular, and then total, solutions can be found in each region and matched at the boundaries. In the situation just described, for example, one would find solutions for $x \leq x_{1}$, for $x_{1} \leq x \leq x_{2}$, and for $x_{2} \leq x$ and would then match them at $x=x_{1}$ and $x=x_{2}$. Furthermore, the solutions for $x \leq x_{1}$ and $x_{2} \leq x$ are just the homogeneous solutions; that is, the particular solutions are zero where the excitation is zero.

Finally, we should note that in many device situations there is no generation, and again the total solution is simply the homogeneous solution adjusted to match the boundary conditions.

### 5.2.3 Boundary Conditions

Equation 5.21 b is a second-order differential equation, and thus our homogeneous solution has two unknown constants. This in turn requires that we have two, and only two, independent boundary conditions in order to determine these two constants. These boundary conditions may be constraints on the excess minority carrier population or on its derivative.

There are a few standard boundary conditions that we will encounter in the course of our work with flow problems in semiconductors.
a) Reflecting boundary. Consider first the boundary condition at the surface of a semiconductor sample in which the minority carrier lifetime is unchanged right up to the surface. Such a boundary is called a reflecting boundary. Electrons and holes cannot normally flow out of a surface, so the boundary condition at a reflecting boundary must be that the carrier fluxes, and currents, there are zero. In particular, the minority carrier current is zero, and consequently the gradient of the excess minority carrier concentration must also be zero at this boundary; that is,

$$
\begin{equation*}
\left.\frac{d n^{\prime}}{d x}\right|_{x=x_{3}}=0 \tag{5.33a}
\end{equation*}
$$

where for the sake of discussion we have assumed a $p$-type sample with a reflecting boundary at $x=x_{3}$. The boundary condition at a reflecting boundary is thus a condition on the excess minority carrier concentration gradient. The excess minority carrier concentration in a sample with a reflecting boundary at $x=w$ is illustrated in Fig. 5.1.


FIGURE 5.1
A $p$-type semiconductor sample with an ohmic contact on the end at $x=0$ and a reflecting boundary on the end at $x=w$.
b) Ohmic contact. At the other extreme from a reflecting boundary (where the minority carrier lifetime is unchanged up to the surface) is an ohmic contact, which is defined as a surface at which the minority carrier lifetime is identically zero.

Assume for the sake of discussion that we have a $p$-type sample with an ohmic contact at $x=x_{4}$. If the minority carrier lifetime at $x=x_{4}$ is zero, then the only way that the term $n^{\prime}\left(x_{4}\right) / \tau_{e}$ can be finite is if $n^{\prime}\left(x_{4}\right)$ is also zero, that is, $n^{\prime}\left(x_{4}\right)=0$. Thus at an ideal ohmic contact, the boundary condition on the excess minority carrier concentration is that it is zero:

$$
\begin{equation*}
n^{\prime}\left(x_{4}\right)=0 \tag{5.33b}
\end{equation*}
$$

The excess minority carrier concentration in a sample with an ohmic contact at $x=0$ is illustrated in Fig. 5.1.

Physically the minority carrier lifetime at and/or near a surface can be made very small, and the ideal ohmic contact boundary condition can be approached, either by putting certain metals on the surface (see App. E) or by introducing additional recombination sites in a thin surface layer by adding certain impurities or by damaging the crystal at the surface.
c) Surface recombination velocity. The ohmic contact and reflecting boundary represent two extremes of a general situation in which some extra recombination may occur at a boundary, but some excess minority carrier population may exist at the same boundary as well. This situation may be described by saying that there is a finite recombination velocity at the surface in question. The amount of recombination occurring at this surface depends on the excess minority carrier
population there and is manifested as a finite flux of carriers "into" the surface. Imagine, for example, that we have a surface at $x=w$ on the right end of a $p$ type semiconductor bar at which the recombination velocity is $s$. Mathematically the boundary condition at $x=w$ in this case is

$$
\begin{equation*}
-\left.D_{e} \frac{d n^{\prime}}{d x}\right|_{x=w}=\operatorname{sn}^{\prime}(w) \tag{5.33c}
\end{equation*}
$$

The general rule is that the flux is into the surface. Thus at the left end of a sample, the negative sign in the above expression becomes a positive sign. To illustrate, suppose that the left end of a $p$-type sample is at $x=0$ and that the surface recombination velocity there is $s$; then, at $x=0$,

$$
\begin{equation*}
\left.D_{e} \frac{d n^{\prime}}{d x}\right|_{x=0}=s n^{\prime}(0) \tag{5.33d}
\end{equation*}
$$

A sample with two surfaces with finite recombination velocities is illustrated in Fig. 5.2.

Notice that the first two boundary conditions we discussed, ohmic contacts and refiecting boundaries, can be viewed as special cases of surfaces with recombination velocities. At an ohmic contact the recombination velocity is infinite, whereas at a reflecting boundary the recombination velocity is zero.
d) Internal boundaries. When we discussed particular solutions in Sec. 5.2.2 we suggested that, when the excitation is not continuous over the length of a sample, it is often desirable mathematically to divide the sample into separate


FIGURE 5.2
A p-type semiconductor sample with surface recombination velocities of $s_{1}$ and $s_{2}$ on the end surfaces at $x=0$ and $x=w$, respectively.


FIGURE 5.3
Internal boundary at $x=x_{5}$ in a $p$-type semiconductor sample, illustrating the continuity of the excess minority carrier concentration and its derivative.
regions and to obtain solutions in each individual region. Boundary conditions then need to be found to relate the various solutions across the boundaries between these regions. Upon examination of Eqs. (5.21b) and (5.23) we see that the minority carrier concentration and its derivative must be continuous across any boundary. A discontinuity in the gradient would imply infinite generation or recombination, whereas a discontinuity in the concentration would imply an infinite current density.

The internal boundary conditions on the excess minority carrier concentration and its derivative are illustrated for a p-type sample in Fig. 5.3.
e) Injecting contacts. A final boundary condition that we will encounter in semiconductor devices is one where either the excess minority carrier population or the minority carrier current is set by conditions external to the sample. It is usually the excess minority carrier population that is constrained, but in either case the boundary condition on the excess minority carrier population or its derivative (i.e., the minority carrier current density) will be obvious.

A word of caution is in order at this point. In order to maintain quasineutrality and to have a quasistatic situation, we must remove at least as much charge as we inject. Thus a sample with an injecting contact at one end must have an ohmic contact at the other, and the two contacts must be connected in some manner through an external circuit, as Fig. 5.4 illustrates. If they are not, the problem will not fit within the class of flow problems.

### 5.2.4 The Total Current

In Sec. 5.1 .6 a procedure was outlined for obtaining the majority carrier current, the electric field, and the excess majority carrier concentration once the excess


FIGURE 5.4
Sample with an injecting contact on one end and an ohmic contact on the other. The current will be determined by the characteristics of the specific injecting contact and the external circuit.
minority carrier concentration and the total current are known. At this point we should make a few additional comments concerning the total current, particularly how we can determine its value.

When ohmic and/or injecting contacts are not on both ends of a sample, or when ohmic contacts are not part of a complete circuit, then the total current is trivially zero.

When there is an injecting contact at one end of a sample and an ohmic contact at the other, the sample must be part of an external circuit; to have a well-specified problem either the total current or the majority carrier current will have to be set by this circuit.

When there are ohmic contacts on both ends of a sample and they are connected through an external circuit, the total current density will simply be related to the voltage difference between the two ohmic contacts by the conductivity of the sample, $\sigma_{o}$ (i.e., by Ohm's law). To obtain this result we begin by adding Eqs. (5.15) and (5.16) to get an equation for $J_{\mathrm{TOT}}$ :

$$
\begin{equation*}
J_{\mathrm{TOT}}=\sigma_{o} \mathscr{E}-q D_{h} \frac{d p^{\prime}}{d x}+q D_{e} \frac{d n^{\prime}}{d x} \tag{5.34}
\end{equation*}
$$

Assume that the sample extends from $x=x_{A}$ to $x=x_{B}$, and integrate $J_{\mathrm{TOT}}$ from one end of the sample to the other:

$$
\begin{equation*}
\int_{x_{A}}^{x_{B}} J_{\mathrm{TOT}} d x=\sigma_{o} \int_{x_{A}}^{x_{B}} \mathscr{E}(x) d x-q D_{h} \int_{x_{A}}^{x_{B}} \frac{d p^{\prime}}{d x} d x+q D_{e} \int_{x_{A}}^{x_{B}} \frac{d n^{\prime}}{d x} d x \tag{5.35}
\end{equation*}
$$

Looking at each term we have

$$
\begin{gather*}
\int_{x_{A}}^{x_{B}} J_{\mathrm{TOT}} d x=J_{\mathrm{TOT}}\left(x_{B}-x_{A}\right)  \tag{5.36a}\\
\sigma_{o} \int_{x_{A}}^{x_{B}} \mathscr{E}(x) d x=\sigma_{o} v_{\mathrm{BA}} \tag{5.36b}
\end{gather*}
$$

$$
\begin{align*}
& q D_{h} \int_{x_{A}}^{x_{B}} \frac{d p^{\prime}}{d x} d x=q D_{h}\left[p^{\prime}\left(x_{B}\right)-p^{\prime}\left(x_{A}\right)\right]=0  \tag{5.36c}\\
& q D_{e} \int_{x_{A}}^{x_{B}} \frac{d n^{\prime}}{d x} d x=q D_{e}\left[n^{\prime}\left(x_{B}\right)-n^{\prime}\left(x_{A}\right)\right]=0 \tag{5.36d}
\end{align*}
$$

The last two integrals are zero because the excess carrier populations must be zero at the two ohmic contacts. Combining these results, we then have our final result:

$$
\begin{equation*}
J_{\mathrm{TOT}}=\sigma_{o} \frac{v_{\mathrm{BA}}}{\left(x_{B}-x_{A}\right)} \tag{5.37}
\end{equation*}
$$

### 5.2.5 Specific Situations

We now have the mathematical models and tools we need to solve flow problems, but our task is still formidable. There is an infinite variety of possible generation functions $g_{L}(x)$, and finding solutions for them is in general very difficult. Fortunately, most of the flow problem situations that are of interest to us in devices-in, for example, $p-n$ diodes and bipolar transistors - can be solved analytically. These situations correspond to cases in which there is (1) uniform injection over all or part of a sample, (2) there is injection only from an injecting contact or boundary, and/or (3) the minority carrier lifetime is infinite (i.e., the minority carrier diffusion length is very long). We will discuss each of these situations and present examples of each, in the following several subsections.

In still other situations, in which it is in general difficult or impossible to get analytical solutions, there are steps we can take to get approximate solutions and thereby gain insight into the full solution. Of course, as well-trained electrical engineers with a full arsenal of analytical techniques for treating linear differential equations and quasi-infinite computational power at our disposal, we can certainly grind out a solution in any complex situation, but we would like to do better. We need methods of getting quick, engineering solutions. We will discuss approximate techniques to do just that after we consider those cases in which we can find analytical solutions.

We are first going to solve for the excess minority carrier population from the quasistatic diffusion equation, which, assuming a $p$-type sample, is

$$
\begin{equation*}
\frac{d^{2} n^{\prime}}{d x^{2}}-\frac{n^{\prime}}{L_{e}^{2}}=-\frac{g_{L}(x)}{D_{e}} \tag{5.38}
\end{equation*}
$$

Then, we can proceed to calculate $J_{e}(x), J_{h}(x), \mathscr{E}(x)$, and $p^{\prime}(x)$.
a) Partially illuminated bar. One situation for which an analytical solution can be obtained is when the generation function has a constant value throughout various regions of the sample. The particular solutions in those regions are then constants. They are equal to the strength of the generation function, say $G$, mul-
tiplied by the minority carrier lifetime $\tau_{\min }$. That is, if $g_{L}(x)$ is $G_{L}$ between $x_{1}$ and $x_{2}$, the particular solution between $x_{1}$ and $x_{2}$ is $G_{L} \tau_{\min }$. The solution for the entire bar is obtained by matching the solutions at the boundaries between the various regions.

## Example

Question. Consider the $p$-type silicon sample of length $w$ illustrated in Fig. 5.5a. The sample end at $x=0$ is a reflecting surface, and there is an ohmic contact at $x=$ $w$. The excitation $g_{L}(x)$ is $G_{L}$ for $0 \leq x \leq x_{1}$ and zero for $x_{1} \leq x \leq w$. Assume that $N_{A}, \mu_{h}, \mu_{e}, D_{h}, D_{e}, \tau_{e}, \tau_{h}$, and the sample dimensions are all specified. What are the excess minority carrier population and minority carrier current in this sample?

Discussion. To find $n^{\prime}(x)$ we first divide the problem into two sections: from $x=0$ to $x=x_{1}$ and from $x=x_{1}$ to $x=w$. We have the following homogeneous solution:

$$
n_{h s}^{\prime}(x)= \begin{cases}A e^{x / L_{e}}+B e^{-x / L_{e}} & \text { for } 0 \leq x \leq x_{1} \\ C e^{x / L_{e}}+D e^{-x / L_{e}} & \text { for } x_{1} \leq x \leq w\end{cases}
$$

The particular solution is

$$
n_{p s}^{\prime}(x)= \begin{cases}G_{L} \tau_{e} & \text { for } 0 \leq x \leq x_{1} \\ 0 & \text { for } x_{1} \leq x \leq w\end{cases}
$$

The total solution is

$$
n^{\prime}(x)= \begin{cases}A e^{x / L_{e}}+B e^{-x / L_{e}}+G_{L} \tau_{e} & \text { for } 0 \leq x \leq x_{1} \\ C e^{x / L_{e}}+D e^{-x / L_{e}} & \text { for } x_{1} \leq x \leq w\end{cases}
$$

The boundary conditions are as follows:

$$
\begin{array}{ll}
\text { At } x=0: & \left.\frac{d n^{\prime}}{d x}\right|_{x=0}=0 \\
\text { At } x=x_{1}: & n^{\prime}\left(x_{1}^{-}\right)=n^{\prime}\left(x_{1}^{+}\right) \\
& \left.\frac{d n^{\prime}}{d x}\right|_{x=x_{1}^{-}}=\left.\frac{d n^{\prime}}{d x}\right|_{x=x_{1}^{+}}
\end{array}
$$

$$
\text { At } x=w: \quad n^{\prime}(w)=0
$$

The only item in this list that we have not discussed already is the particular solution for $x$ between 0 and $x_{1}$. There are several points to keep in mind about particular solutions. The first is that they are unique. Thus we can be confident that if we find a solution that works, it will be the only one. The second point is that particular solutions in general take the same shape, or functional form, as the excitation. Thus a good first guess is a function that looks like the excitation. In


FIGURE 5.5
(a) A uniformly doped, p-type silicon bar with a reflecting boundary on one end and an ohmic contact on the other; $(b)$ uniform illumination between $x=0$ and $x=x_{1}$ and zero illumination elsewhere; $(c)$ solution for $n^{\prime}(x)$; (d) solution for $J_{e}(x)$.
this case we guess a constant value, or if that doesn't work, a polynomial. In the present problem, a constant value works just fine.

We have four constants to determine by fitting the total solution to the boundary conditions. We have four independent boundary conditions, which give us four equations in our four unknowns, $A, B, C$, and $D$. Their solution requires an algebraic tour de force and teaches us little except that we can get a solution if we really have to. For the record, the results are

$$
\begin{gathered}
A=B=\frac{G_{L} \tau_{e}}{2} \cosh \left(\frac{x_{1}}{L_{e}}\right)\left\{\tanh \left(\frac{x_{1}}{L_{e}}\right)-\tanh \left[\frac{\left(x_{1}-w\right)}{L_{e}}\right]\right\} \\
C=-e^{-2 w / L_{e}} D=A e^{-w / L_{e}} \frac{\sinh \left(x_{1} / L_{e}\right)}{\cosh \left[\left(x_{1}-w\right) / L_{e}\right]}
\end{gathered}
$$

The corresponding $n^{\prime}(x)$ is plotted in Fig. 5.5c, and the minority carrier current density $J_{e}(x)$ is plotted in Fig. $5.5 d$. We see that the minority carrier population is highest where there is generation and then drops off toward the ohmic contact. The electron flux $J_{e}(x) / q$ builds up due to the generation, from zero at $x=0$ to a peak at $x=x_{1}$, and then decreases from $x_{1}$ to $w$ as some of the electrons recombine with holes.

Rather than proceeding to obtain $J_{h}(x), \mathscr{E}(x)$, and $p^{\prime}(x)$ in the above example, we will leave this problem and move on to some additional special situations that will give us more insight into solutions for flow problems.
b) Impulse illumination. Another important situation is that in which the generation function is a spatial impulse. As we shall see by looking at an example, in this situation the generation function is zero almost everywhere and the solution is simply the homogeneous solution. The role of the generation is to impose new boundary conditions at the position(s) of the impulse(s). Impulse generation is of particular importance to us because if we know the impulse response of a linear system, such as we have in flow problems, then we can get the response to any arbitrary generation function.

## Example

Question. Imagine that all of the generation in the sample pictured in Fig. $5.5 a$ is concentrated very near the end at $x=0$. Mathematically, consider the limit as $x_{1}$ goes to zero, but at the same time you reduce $x_{1}$, increase $G_{L}$ in such a manner that the product $G_{L} x_{1}$ remains constant and equal to $M$. In this limit, $g_{L}(x)$ becomes an impulse at $x=0$ of intensity $M \mathrm{~cm}^{-2} \mathrm{~s}^{-1}$, as is illustrated in Figs. 5.6a and $b$. What are $n^{\prime}(x)$ and $J_{e}(x)$ in this situation?

Discussion. We could get a solution by taking the appropriate limit of the solution we just obtained for a bar with illumination from 0 to $x_{1}$, but we will instead take another approach. We recognize that as $x_{1}$ becomes very small we will inevitably be in the limit $x_{1} \ll L_{e}$, and thus in the region $0 \leq x \leq x_{1}$, $L_{e}$ will always be much larger than $x$. Thus on the size scale with which


FIGURE 5.6
(a) A $p$-type semiconductor bar; (b) impulse illumination at $x=0$; (c) solution for $n^{\prime}(x)$ : and (d) solution for $J_{e}(x)$.
we are dealing, $L_{e}$ is effectively infinite, and once we can assume that $L_{e}$ is infinite, Eq. (5.21b) immediately simplifies to Eq. (5.32b):

$$
\frac{d^{2} n^{\prime}}{d x^{2}}=-\frac{g_{L}(x)}{D_{e}}=-\frac{G_{L}}{D_{e}}
$$

for $0 \leq x \leq x_{1}$. Integrating twice, we obtain directly the total solution for $n^{\prime}(x)$ for $0 \leq x \leq x_{1}$. (For a more thorough discussion of this method of solving for $n^{\prime}(x)$, see subsection $d$ below.) Thus our total solution for all $x$ becomes

$$
n^{\prime}(x)=\left\{\begin{array}{cl}
-\frac{G_{L} x^{2}}{2 D}+A x+B & \text { for } 0 \leq x \leq x_{1} \\
C e^{x / L_{e}}+D e^{-x / L_{e}} & \text { for } x_{1} \leq x \leq w
\end{array}\right.
$$

Applying our boundary conditions to these expressions, we find first that $A=0$ from the boundary condition at $x=0$. Second, from the condition at $x=w$, we find that

$$
C e^{w / L_{e}}+D e^{-w / L_{e}}=0
$$

Next, by matching $n^{\prime}$ at $x=x_{1}$, we obtain

$$
-\frac{G_{L} x_{1}^{2}}{2 D_{e}}+B=C e^{x_{1} / L_{e}}+D e^{-x_{1} / L_{e}}
$$

which, in the limit $x_{1} \rightarrow 0$ and $G_{L} \rightarrow \infty$ such that $G_{L} x_{1}=M$, is

$$
B=C+D
$$

Finally, by matching $d n^{\prime} / d x$ at $x_{1}$ we obtain

$$
-\frac{G_{L} x_{1}}{D_{e}}=\frac{C e^{x_{1} / L_{e}}-D e^{-x_{1} / L_{e}}}{L_{e}}
$$

which in our limit is

$$
-\frac{M}{D_{e}}=\frac{(C-D)}{L_{e}}
$$

Solving for $C$ and $D$ we obtain our total solution

$$
n^{\prime}(x)=\frac{M L_{e}}{D_{e}} \frac{e^{(w-x) / L_{e}}-e^{-(w-x) / L_{e}}}{e^{w / L_{e}}+e^{-w / L_{e}}} \quad \text { for } 0 \leq x \leq w
$$

This can also be written as

$$
n^{\prime}(x)=\frac{M L_{e}}{D_{e}} \frac{\sinh \left[(w-x) / L_{e}\right]}{\cosh \left(w / L_{e}\right)} \quad \text { for } 0 \leq x \leq w
$$

(Note that since we have let $x_{1}$ go to zero, the region $0 \leq x \leq x_{1}$ no longer exists.)
The electron current density is

$$
J_{e}(x)=-q M \frac{\cosh \left[(w-x) / L_{e}\right]}{\cosh \left(w / L_{e}\right)} \quad \text { for } 0 \leq x \leq w
$$

You will note that $J_{e}(0)=-q M$. This result might at first seem to be inconsistent with having a reflecting surface at $x=0$, but everything is proper because with our impulse illumination we are injecting $M$ hole-electron pairs right at the surface at $x=0$. These carriers diffuse away, giving an electron flux at $x=0$ of $M$, or a current density of $-q M$.

The expressions we have found for $n^{\prime}(x)$ and $-J_{e}(x)$ are plotted in Figs. 5.6c and $d$, respectively.

In the above example, the impulse occurred at the end of the sample. If it were to occur within the bulk of the sample, the injected carriers would in general diffuse both to the left and to the right. The boundary conditions at the position of the impulse are then (1) that the excess minority carrier population will be continuous and (2) that there will be a discontinuity in the minority carrier current density equal to the strength of the impulse multiplied by the minority carrier charge (which is $-q$ for electrons, $+q$ for holes).
c) Injecting contacts. The above example in which there was impulse generation at one end of a sample corresponds to the situation that arises when there is an injecting contact at one end of a sample. This situation is extremely important to us because it is what occurs in junction devices (e.g., p-n diodes and bipolar transistors).

Refer to Fig. 5.6a. If instead of an impulse of light at $x=0$ we had an injecting contact at the same point that was injecting $M$ electrons $/ \mathrm{cm}^{2} \cdot \mathrm{~s}$, the solutions for $n^{\prime}(x)$ and $J_{e}(x)$ would be unchanged. The injecting contact, as we have specified it, imposes exactly the same boundary condition as did the impulse generation function.

Another way of specifying an injecting contact is to say that it fixes the excess minority carrier population at the contact. That is, in our example, we might have specified that the injecting contact at $x=0$ maintains $n^{\prime}(0)$ at some value, say $N^{\prime}$. The shapes of the $n^{\prime}(x)$ and $J_{e}(x)$ profiles would be the same as they were previously, but the magnitudes would be different, depending now on the value of $N^{\prime}$.

## Example

Question. Consider a sample identical to that pictured in Fig. 5.6a except that it has an injecting contact at $x=0 ; g_{L}(x)$ is identically zero. The injecting contact establishes $n^{\prime}(0)=N^{\prime}$. What are $n^{\prime}(x)$ and $J_{e}(x)$ ?

Discussion. The total solution for $n^{\prime}(x)$ is just the homogeneous solution with the two constants chosen to fit the boundary conditions, namely $n^{\prime}(0)=N^{\prime}$ and $n^{\prime}(w)=0$. Thus we have

$$
n^{\prime}(x)=A e^{x / L_{e}}+B e^{-x / L_{e}}
$$

Applying the boundary condition constraints tells us that

$$
A+B=N^{\prime}
$$

and

$$
A e^{w / L_{e}}+B e^{-w / L_{e}}=0
$$

from which we can easily solve for $A$ and $B$.
By now, however, we should start being more clever in our solutions. Specifically, we know that the homogeneous solutions can be written as combinations of sinh and cosh functions, and we know certain properties of sinh and cosh. We know, for instance, that a sinh function can have a zero value and thus could be chosen to solve the boundary conditions. A little thought should convince you that the solution we seek for $n^{\prime}(x)$ is

$$
n^{\prime}(x)=N^{\prime} \frac{\sinh \left[(w-x) / L_{e}\right]}{\sinh \left(w / L_{e}\right)}
$$

If this is not "obvious" to you, and it may well not be, you should be able to solve for $A$ and $B$ above and arrive at the same result. Having $n^{\prime}(x)$, we can immediately find $J_{e}(x)$ :

$$
J_{e}(x)=-\frac{q D_{e} N^{\prime}}{L_{e}} \frac{\cosh \left[(w-x) / L_{e}\right]}{\sinh \left(w / L_{e}\right)}
$$

Comparing these results with those we obtained for impulse excitation will show you that the shapes are identical and that only the magnitudes are different. [The magnitudes differ only because the boundary condition in this case was on $n^{\prime}(x)$, whereas in the earlier case it was on $J_{e}(x)$.]

Two special cases of samples with one injecting contact are those in which the sample is either very long or very short. By very long we mean that the ohmic contact on the other end of the sample is many minority carrier diffusion lengths away from the injecting contact (i.e., $w \gg L_{e}$, where $w$ is the length of the sample). By very short we mean the opposite (i.e., $w \ll L_{e}$ ).

In the case of a very long device, which we will refer to as the long-base limit, the profiles are single decaying exponentials falling away from the injecting contact. All of the excess minority carriers injected at the contact recombine well before they reach the ohmic contact, and the minority carrier current drops to zero well before the ohmic contact.

## Example

Question. Consider a $p$-type sample like that discussed above with an injecting contact at $x=0$ injecting $M$ electrons $/ \mathrm{cm}^{2} \cdot \mathrm{~s}$, with an ohmic contact at $x=w$, and in which $L_{e}$ is much smaller than $w$ (i.e., $L_{e} \ll w$ ). What are $n^{\prime}(x)$ and $J_{e}(x)$ in this sample?

Discussion. In the limit $w \gg L_{e}$, our solutions for impulse injection at $x=0$ are

$$
n^{\prime}(x) \approx \frac{M L_{e}}{D_{e}} e^{-x / L_{e}}
$$

and

$$
J_{e}(x) \approx-q M e^{-x / L_{e}}
$$

These results are plotted in Figs. $5.7 a$ and $b$. We see that the excess holes and electrons generated at $x=0$ all recombine well before they reach the ohmic contact. Consequently the electron current has also gone to zero well before $x=w$.

In the other extreme, that of very short devices, which we will refer to as the short-base limit, we have the situation we discussed in Sec. 5.2.1 that corresponds to an essentially infinite minority carrier lifetime. The solution for $n^{\prime}(x)$ in a sample with an injecting contact on one end and an ohmic contact on the other is a straight line that decreases from a finite value at the injecting contact to zero at the ohmic contact. The minority carrier current is constant throughout the sample because there is essentially no recombination in the sample and almost every excess minority carrier injected at the contact flows through the sample to the ohmic contact, where it recombines.

## Example

Question. Consider a $p$-type sample like that discussed above with an injecting contact at $x=0$ injecting $M$ electrons $/ \mathrm{cm}^{2} \cdot \mathrm{~s}$, with an ohmic contact at $x=w$, and in which $L_{e}$ is much greater than $w$ (i.e., $L_{e} \gg w$ ). What are $n^{\prime}(x)$ and $J_{e}(x)$ in this sample?

Discussion. In the limit $w \ll L_{e}$, our solutions are

$$
n^{\prime}(x) \approx \frac{M}{D_{e}}(w-x)
$$

and

$$
J_{e}(x)=-q M
$$

These results are plotted in Figs. $5.7 c$ and $d$. Note that now $n^{\prime}(x)$ decreases linearly to zero at $x=w$, as we said it would, and note that $J_{e}(x)$ is constant between 0 and $w$. This is because having $L_{e} \gg w$ is equivalent to an extremely long minority carrier lifetime. This in turn implies that very little recombination occurs in the sample (except, of course, at the ohmic contact, where essentially all of the excess hole-electron pairs recombine).

We say that "essentially none" of the carriers injected at the contact recombine in a sample in the short-base/infinite lifetime limit because very little recombination occurs and for purposes of calculating $n^{\prime}(x)$ and $J_{e}(x)$ we can ignore it. At the same time, it is important to realize that if we ever really need to know how much recombination occurs we can readily estimate it. To do so we simply notice that the recombination occurring at any point $x$ is $n^{\prime}(x) / \tau_{e}$. Thus,


FIGURE 5.7
Minority carrier concentration and current density, respectively, as functions of position in a $p$-type silicon bar with a contact injecting $M$ electrons $/ \mathrm{cm}^{2} \cdot \mathrm{~s}$ at $x=0:(a$ and $b)$ for $L_{e} \ll w$; ( $c$ and $d$ ) for $L_{e} \gg w$.
the total recombination per unit area occurring between 0 and $w$ is

$$
\begin{equation*}
F_{R}=\int_{0}^{w} \frac{n^{\prime}(x)}{\tau_{e}} d x \tag{5.39}
\end{equation*}
$$

which in the case considered in the last example is

$$
\begin{equation*}
F_{R}=\frac{M w^{2}}{2 D_{e} \tau_{e}}=M \frac{w^{2}}{2 L_{e}^{2}} \tag{5.40}
\end{equation*}
$$

Of the total number $M$ of hole-electron pairs unit area that were generated at $x=0$, a fraction equal to $w^{2} / 2 L_{e}^{2}$ recombine between 0 and $w$; the rest recombine at the contact. Clearly, when $L_{e} \gg w$, a very small fraction recombine because $w^{2} / L_{e}^{2}$ is a very small number.

Repeating this exercise for the case $L_{e} \ll w$, we find that

$$
\begin{equation*}
F_{R}=\int_{0}^{w} \frac{n^{\prime}(x)}{\tau_{e}} d x=M \tag{5.41}
\end{equation*}
$$

Now all of the hole-electron pairs generated at $x=0$ recombine in the sample, and none recombine at the ohmic contact, which is just what we had concluded earlier by looking at the electron current.
d) Infinite lifetime solutions. We have mentioned that in short samples, where "short" implies small relative to the minority carrier diffusion length, the quasistatic diffusion equation reduces to

$$
\begin{equation*}
\frac{d^{2} n^{\prime}}{d x^{2}}=-\frac{g_{L}(x)}{D_{e}} \tag{5.32}
\end{equation*}
$$

This situation is often referred to as the infinite lifetime approximation because the same result is obtained in the limit $\tau_{e} \rightarrow \infty$ and, more physically, because the term that has dropped out of the equation is the recombination term $n^{\prime} / \tau_{e}$ (actually, $n^{\prime} / L_{e}^{2}$ ). No recombination implies infinite lifetime.

It is not necessary to find homogeneous and particular solutions to solve Eq. (5.32). Doing so works, but it is far easier to simply integrate twice; the boundary conditions are then used to determine the two constants of integration.

## Example

Question. Consider a $p$-type sample of length $w$ with ohmic contacts on each end (i.e., at $x=0$ and at $x=w$ ). The minority carrier lifetime in this sample is sufficiently long that $L_{e} \gg w$, and it is illuminated by light generating $g_{L}(x)$ carriers $/ \mathrm{cm}^{3} \cdot \mathrm{~s}$. What are $n^{\prime}(x)$ and $J_{e}(x)$ ?

Discussion. Integrating Eq. (5.32) yields

$$
\frac{d n^{\prime}}{d x}=-\frac{1}{D_{e}} \int_{0}^{x} g_{L}\left(x^{\prime}\right) d x^{\prime}+A
$$

and integrating again yields

$$
n^{\prime}(x)=-\frac{1}{D_{e}} \int_{0}^{x} \int_{0}^{x^{\prime}} g_{L}\left(x^{\prime \prime}\right) d x^{\prime \prime} d x^{\prime}+A x+B
$$

We now must use the boundary conditions to evaluate the two constants of integration, $A$ and $B$. In this example the sample has ohmic contacts on both ends, so the boundary conditions are that $n^{\prime}(0)$ and $n^{\prime}(w)$ are zero. Imposing these conditions, we find from the condition at $x=0$ that $B$ is zero; from the condition at $x=w$ we find that $A$ is given as

$$
A=\frac{1}{D_{e} w} \int_{0}^{w} \int_{0}^{x^{\prime}} g_{L}\left(x^{\prime \prime}\right) d x^{\prime \prime} d x^{\prime}
$$

If the boundary conditions had been on the current, that is, if we had had injecting contacts and/or reflecting boundaries, then we would have had to use our solution for the gradient of $n^{\prime}$ to evaluate one or more of the constants.
e) Finite lifetime solutions. The observation that it is relatively easy to find $n^{\prime}(x)$ when the lifetime is infinite leads us to suggest a convenient method of estimating the solution in situations where the assumption of an infinite lifetime is not valid and where finding the particular solution proves difficult or impossible. In such cases we can first assume that the lifetime is infinite and get the solution by integrating $g_{L}(x)$ twice as we have shown. We can then "adjust" this solution for the fact that the lifetime is finite by letting the infinite lifetime solution "sag" appropriately. To appreciate what this means, compare Figs. 5.7a (short lifetime), $5.6 c$ (moderate lifetime), and $5.7 c$ (infinite lifetime). The increasing "sag" in the profile with decreasing lifetime is quite graphic. Fig. 5.8 summarizes these observations.
f) Superposition. The diffusion equation is a linear differential equation, so the response to a sum of excitations is equal to the sum of the responses to the individual excitations. We can thus use superposition to solve flow problems. An example is illustrated in Fig. 5.9.

Keep in mind, however, that the total solution must satisfy our assumptions: it is not enough that the individual parts alone each satisfy the assumptions. Thus, for example, the total $n^{\prime}$ must be much less than $p_{o}$ for low-level injection to be a valid assumption. It is not enough for $n^{\prime}$ due to each individual excitation to satisfy this condition.

### 5.2.6 The Currents, Electric Field, and Net Charge

Thus far we have concentrated on the problem of finding the excess minority carrier concentration, and rightly so, because that is the difficult part. Once this concentration is known, finding the currents, electric field, and net charge is more


FIGURE 5.8
Illustration of the "sag" in $n^{\prime}(x)$ as the lifetime is decreased: (a) assuming constant injected flux; (b) assuming constant $n^{\prime}(0)$.


FIGURE 5.9
Illustration of superposition. Note that $n^{\prime}(x)$ need not consist of straight lines for superposition to be valid.
or less mechanical. Nonetheless, we can still make some general comments on the majority carrier current, the electric field, and the net charge density (from which we determine the excess majority carrier concentration) that can help you develop some insight with respect to these quantities.

First, we note that the spatial variation of the majority carrier current density mirrors that of the minority carrier current density. Since the sum of the two currents is a constant, $J_{\mathrm{TOT}}$, when one increases the other must decrease and vice versa. Physically, when the magnitude of the current changes, there is hole-electron pair generation or recombination. If, for example, the hole current density increases going from left to right, holes are being added to the flux stream, so there must be net generation in that region. Correspondingly, the electron current density will decrease going from left to right because more negative charge is simultaneously being added to the stream. If, on the other hand, the hole current is decreasing, holes are disappearing (i.e., recombining) in that region. At the
same time the electron flux must also be decreasing, implying an increase in the electron current. The two fluxes must change in concert.

Second, we note that the shape of the electric field reflects that of the currents. This can easily be seen by referring to Eq. (5.26), but we can go further with the help of a bit of algebraic manipulation. Assuming that we have a $p$-type sample, we can show that the electric field can be written as either

$$
\begin{equation*}
\mathscr{E}(x)=\frac{J_{\mathrm{TOT}}-\left[1-\left(D_{h} / D_{e}\right)\right] J_{e}(x)}{q \mu_{h} p_{o}} \tag{5.42}
\end{equation*}
$$

or

$$
\begin{equation*}
\mathscr{E}(x)=\frac{D_{h}}{D_{e}} \frac{J_{\mathrm{TOT}}+\left[\left(D_{e} / D_{h}\right)-1\right] J_{h}(x)}{q \mu_{h} p_{o}} \tag{5.43}
\end{equation*}
$$

Realizing that $D_{h}<D_{e}$ in the typical semiconductor, we see that the shape of the electric field is the same as that of the hole current (offset by a constant amount proportional to $J_{\text {TOT }}$ ). Physically this results from the fact that the electrons diffuse more quickly than the holes, so the electric field that develops to maintain charge neutrality must be such that it pushes holes in the direction of any concentration gradients. Thus the hole drift and diffusion currents are codirectional.

The same conclusion is reached even if the sample is $n$-type. A bit of algebra tells us that in an $n$-type sample the field is

$$
\begin{equation*}
\mathscr{E}(x)=\frac{J_{\mathrm{TOT}}+\left[1-\left(D_{h} / D_{e}\right)\right] J_{h}(x)}{q \mu_{e} n_{o}} \tag{5.44}
\end{equation*}
$$

Comparing this result with that for the $p$-type sample above reveals that the forms are identical. The two results do differ in magnitude, however. If we compare samples with identical doping levels (i.e., majority carrier concentrations), the field in the $p$-type sample is larger by a factor of $D_{e} / D_{h}$ (or, equivalently, $\mu_{e} / \mu_{h}$ ). This simply reflects the fact that less field is needed to adjust the majority carrier population in an $n$-type sample than in a $p$-type sample because electrons drift more readily than holes.

Finally, we note that we can show that the net charge is directly proportional to the net generation of hole-electron pairs. Assuming a $p$-type sample, we use our expression above for $\mathscr{E}(x)$, Eq. (5.42), in Poisson's equation, Eq. (5.19), to write the net charge density $\rho(x)$, which equals $q\left[p^{\prime}(x)-n^{\prime}(x)\right]$, as

$$
\begin{equation*}
\rho(x)=\varepsilon \frac{d \mathscr{E}(x)}{d x}=\frac{\varepsilon}{q \mu_{h} p_{o}} \frac{d}{d x}\left[J_{\mathrm{TOT}}-\left(1-\frac{D_{h}}{D_{e}}\right) J_{e}(x)\right] \tag{5.45}
\end{equation*}
$$

Using the fact that $J_{\mathrm{TOT}}$ is not a function of $x$ and that $J_{e}(x)$ can be written as $q D_{e}\left(d n^{\prime} / d x\right)$, we arrive at

$$
\begin{equation*}
\rho(x)=-\varepsilon \frac{\left(D_{e}-D_{h}\right)}{\mu_{h} p_{o}} \frac{d^{2} n^{\prime}}{d x^{2}} \tag{5.46}
\end{equation*}
$$

Note that $d^{2} n^{\prime} / d x^{2}$ is proportional to the negative of the net generation, that is, $-\left[g_{L}(x)-n^{\prime} / \tau_{e}\right]$ [see Eq. (5.21a)], so we have

$$
\begin{equation*}
\rho(x)=\varepsilon \frac{\left(D_{e}-D_{h}\right)}{\mu_{h} p_{o} D_{e}}\left[g_{L}(x)-\frac{n^{\prime}}{\tau_{e}}\right] \tag{5.47}
\end{equation*}
$$

We could pursue this line of discussion further and reach additional conclusions on quasineutrality, but that would be too much detail for now. It is important to realize that $\rho(x)$ should look like the net generation, particularly when $\tau_{e}$ is very large, and that you can use this fact as a check on your answer when you are calculating $\rho(x)$.

One last point to make is that if we differentiate the electric field and solve Poisson's equation for $\rho(x)$, we find an impulse of negative charge at an ohmic contact (assuming that excess carriers diffuse that far and recombine there) because the electric field drops immediately to zero at the contact. This is totally consistent with Eq. (5.47) because there is infinite recombination at an ohmic contact, but it is hard to reconcile with the assumption of quasineutrality. The problem stems from our modeling of the ohmic contact and the fact that things are happening very quickly (spatially) there. Our model for an ohmic contact is itself an approximation in which we assume that the recombination becomes infinite at the contact. If we use a more physically realistic model that had the recombination occur over a small but finite distance, we can avoid having infinite recombination, but our model needlessly becomes much more complex. We probably still could not apply our quasineutrality assumption in such a thin region because the region would be small relative to an extrinsic Debye length. However, we do not need to know in detail what goes on in the contact. The situation is very much like the case of impulse injection. Furthermore, if we intend to simplify our modeling task by ignoring what goes on in detail in the contact and assume infinite recombination, then we should not be disturbed if our model seems to predict other nonphysical results. One of the lessons of modeling is learning when to worry about nonphysical results (i.e., when they indicate serious problems with the model) and when not to worry about them (i.e., when they are artifacts that are harmless and can be ignored).

### 5.3 SUMMARY

In this chapter we have considered situations in which one particular set of assumptions concerning a semiconductor is valid, and we have learned how to determine the excess carrier concentrations, the various current densities, and the electric field in such situations. We have seen that when we can assume that we are dealing with uniformly doped, extrinsic material under low-level quasistatic excitation, and when quasineutrality is valid and the minority carrier drift current is negligible, then the five coupled nonlinear differential equations we developed in Chap. 4 to describe semiconductors in general can be simplified to one secondorder linear differential equation for the excess minority carrier concentration (we assume a $p$-type sample for the purposes of our discussion):

$$
\frac{d^{2} n^{\prime}}{d x^{2}}-\frac{n^{\prime}}{L_{e}^{2}}=-\frac{g_{L}(x)}{D_{e}}
$$

where $L_{e}$ is the minority carrier diffusion length given by $\sqrt{D_{e} \tau_{e}}$. Since this is a second-order differential equation, there are two unknown parameters in the solution and two boundary conditions are needed to determine them. We have discussed several common boundaries we might encounter, including ohmic contacts, reflecting boundaries, and injecting contacts, as well as internal boundaries. We have labeled this special class of problems as flow problems, and we have discussed their solution in a variety of situations.

A particularly important situation for device analysis occurs when the minority carrier diffusion length $L_{e}$ is very large compared to the size of the sample. In this situation, which is referred to either as the infinite lifetime case or the short-base limit, the factor $n^{\prime} / L_{e}^{2}$ is negligible and our equation becomes

$$
\frac{d^{2} n^{\prime}}{d x^{2}}=-\frac{g_{L}(x)}{D_{e}}
$$

This equation can be solved by integrating twice; again two boundary conditions are needed, this time to evaluate the two constants of integration.

Once the excess minority carrier concentration is known, we have seen that it is relatively easy to determine the currents, the electric field, and the net charge density, from which we calculate the excess majority carrier concentration. One other factor that we do need to determine, however, is the total current density $J_{\text {TOT }}$, but we have seen that this is just a constant and that it is in general possible to determine its value from the problem specifications.

As a practical matter, we will find when we discuss devices that 90 percent of the flow problems in devices are one of two types: low-level injection at one end of a bar, and arbitrary low-level excitation of a bar with infinite lifetime (or minority carrier diffusion length). In the first instance the excess minority carrier distributions look like those in Fig. 5.8, and are given by

$$
n^{\prime}(x)=\frac{M L_{e}}{D_{e}} \frac{\sinh \left[(w-x) / L_{e}\right]}{\cosh \left(w / L_{e}\right)}
$$

where we have assumed that we have a $p$-type sample with an injecting contact at $x=0$ injecting $M$ electrons $/ \mathrm{cm}^{2} \cdot \mathrm{~s}$ and an ohmic contact at $x=w$. In the second instance the excess minority carrier concentration is found by integrating the generation function:

$$
n^{\prime}(x)=\frac{1}{D_{e}} \int_{0}^{x} \int_{0}^{x^{\prime}} g_{L}\left(x^{\prime \prime}\right) d x^{\prime \prime} d x^{\prime}+A x+B
$$

The constants $A$ and $B$ are determined by fitting the boundary conditions.

## PROBLEMS

5.1 Consider the $p$-type silicon sample ( $p_{o}=10^{17} \mathrm{~cm}^{-3}$ ) shown in Fig. P5.1 in which the minority carrier lifetime is zero in the portion $x<0$ and is $10^{-4} \mathrm{~s}$ elsewhere.


FIGURE P5.1

The sample is illuminated with light, creating an excess minority carrier population of $10^{15} \mathrm{~cm}^{-3}$ across the plane at $x=L_{e} / 10$, where $L_{e}$ is the minority carrier diffusion length.
(a) What is $n^{\prime}(x)$ ? Give three expressions valid in each of the regions $x \leq 0,0 \leq$ $x \leq L_{e} / 10$, and $L_{e} / 10 \leq x$. Sketch your answer.
(b) What is the optical hole-electron pair generation rate in the plane $x=L_{e} / 10$ ?
5.2 This problem concerns the $p$-type silicon bar of length $w$ illustrated in Fig. P5.2a. There are ohmic contacts on each end of the bar. $N_{A}=5 \times 10^{17} \mathrm{~cm}^{-3}, \mu_{e}=1500$ $\mathrm{cm}^{2} / \mathrm{V} \cdot \mathrm{s}, \mu_{h}=600 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}$, and the minority carrier lifetime is $6 \times 10^{-5} \mathrm{~s}$. You may assume that the minority carrier diffusion length is much greater than $w$ (i.e., $\left.L_{e} \gg w\right)$.

The bar is illuminated by a constant light (i.e., $d g_{L} / d t=0$ ) in such a way that the electron current density is as illustrated in Fig. P5.2b.

Assume that low-level injection and quasineutrality are both valid assumptions.
(a) Sketch and dimension the hole current $J_{h}(x)$ for $0 \leq x \leq w$, being careful to indicate its values at $x=0, w / 2$, and $w$.
(b) (i) What is the ratio of the electron diffusion current density at $x=w / 4$ to the hole diffusion current density at $x=w / 4$ ?
(ii) What is the ratio of the electron drift current density at $x=w / 4$ to the hole drift current density at $x=w / 4$ ?


FIGURE P5.2a


FIGURE P5.2b
(c) Sketch and dimension (i) the electric field and (ii) the net charge density for $0 \leq x \leq w$.
(d) Sketch and dimension the excess electron concentration $n^{\prime}(x)$, for $0 \leq x \leq w$, being careful to indicate its values at $x=0$ and $w$, and the shape of $n^{\prime}(x)$.
(e) Sketch and dimension the optical generation rate $g_{L}(x)$ for $0 \leq x \leq w$. Specify the peak value of $g_{L}(x)$.
5.3 Consider the uniform p-type sample illustrated in Fig. P5.3 for which $L_{e} \gg L$. It is uniformly illuminated for $L / 3 \leq x \leq 2 L / 3$ with light that generates $G_{L}$ hole-electron pairs $/ \mathrm{cm}^{3} \cdot \mathrm{~s}$ in the bulk. One end of the sample has an ohmic contact, the other has a reffecting boundary.

Assume that low-level injection, quasineutrality, and minority carrier flow by diffusion are valid assumptions. Assume room temperature also.

Sketch and dimension the following quantities:
(a) $n^{\prime}(x)$
(b) $J_{e}(x)$
(c) $J_{h}(x)$
(d) ${ }^{6}(x)$
(e) $p^{\prime}(x)-n^{\prime}(x)$
5.4 Consider the uniform $n$-type ( $N_{d}=10^{17} \mathrm{~cm}^{-3}$ ) silicon sample illustrated in Fig. P5.4. The two light sources at $x=L / 3$ and $x=2 L / 3$ are identical and each generate $10^{15}$ hole-electron pairs $/ \mathrm{cm}^{2} \cdot \mathrm{~s} . L=10^{-4} \mathrm{~cm}$.


FIGURE P5.3


FIGURE P5.4
(a) (i) Assume that $L_{h} \gg L$, and find $p^{\prime}(x)$.
(ii) Sketch and dimension your result.
(iii) On your sketch indicate $p^{\prime}(x)$ due to $M_{1}$ alone illuminating the sample and $p^{\prime}(x)$ due to $M_{2}$ alone illuminating the sample.
(iv) Indicate whether superposition is valid.
(b) Assume that $L_{h}$ is no longer much greater than $L$, but rather that the two are comparable. Make a rough sketch of $p^{\prime}(x)$ now, indicating how the shapes and peak values change relative to those corresponding to part a.
5.5 Consider the uniformly doped $p$-type sample illustrated in Fig. P5.5a, which has ohmic contacts on both ends and is open-circuited. The doping level is $10^{16} \mathrm{~cm}^{-3}$, $D_{e}=40 \mathrm{~cm}^{2} / \mathrm{s}, D_{h}=10 \mathrm{~cm}^{2} / \mathrm{s}$, and the minority carrier diffusion length is much greater than $L$ (i.e., $L_{e} \gg L$ ).

The sample is illuminated nonuniformly in such a manner that the electron current density is as plotted in Fig. P5.5b.

Sketch and label the following quantities for $0 \leq x \leq L$ :
(a) Hole current density $J_{h}(x)$
(b) Excess electron density $n^{\prime}(x)$
(c) Electric field, $\mathscr{E}(x)$
(d) Generation function $g_{L}(x)$.
(e) Net charge density $\rho(x)$.


FIGURE P5.5a


## FIGURE P5.5b

5.6 The uniformly doped $p$-type $\left(N_{a}-N_{d}=10^{17} \mathrm{~cm}^{-3}\right.$ ) Si sample of length $L=6 \mu \mathrm{~m}$ and cross section $0.1 \mathrm{~cm}^{2}$ with ohmic contacts on each end illustrated in Fig. P5.6 is illuminated by light, with the resultant excess electron population also shown.

Assume the following for silicon at room temperature: $\mu_{e}=1500 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}$, $\mu_{h}=600 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}, n_{i}=1.0 \times 10^{10} \mathrm{~cm}^{-3}$. Assume also that $L_{e} \gg 6 \mu \mathrm{~m}$.
(a) What are the diffusion coefficients $D_{e}$ and $D_{h}$ in this sample?
(b) If it is known that the minority carrier diffusion length in this sample is $60 \mu \mathrm{~m}$, what is the minority carrier lifetime?


FIGURE P5.6
(c) Sketch and dimension the following quantities assuming $L_{e} \gg 6 \mu \mathrm{~m}$.
(i) Electron current density $J_{e}(x)$.
(ii) Total current density $J_{\mathrm{TOT}}(x)$.
(iii) Hole current density $J_{h}(x)$.
(iv) Optical generation function $g_{L}(x)$.
(d) Using the value you found in Part (b) for $\tau_{e}$, calculate the total recombination occurring within this sample between $\mathrm{x}=0^{+}$and $\mathrm{x}=2$. (Note: The units of your answer should be hole-electron pairs per second.)
5.7 We argue that it is very difficult to maintain charge imbalances for long times or over long distances in an extrinsic semiconductor, and thus that the material tends to stay electrically neutral (we call it quasineutral). The relevant time factor is the dielectric relaxation time; the relevant distance factor is the Debye length (see App. D). This problem deals with dielectric relaxation time.
(a) A macroscopic example of dielectric relaxation is the decay of charge stored on a "leaky capacitor." Such a capacitor might be a parallel plate capacitor having a conducting dielectric (i.e., one with a dielectric constant $\varepsilon$ and a nonzero conductivity $\sigma$ ). A "leaky capacitor" can be modeled as an ideal capacitor in parallel with an ideal resistor.
(i) Show that the charge stored on a capacitor of capacitance $C$ in parallel with a resistor of resistance $R$ will delay as

$$
q(t)=Q_{o} e^{-t / R C}
$$

if the charge at $t=0$ is $Q_{0}$.
(ii) Find an expression for the resistance $R$ of a leaky capacitor with plate area $A$ and plate separation $d$.
(iii) Find an expression for the capacitance $C$ of the same leaky capacitor as in part ii.
(iv) Find an expression for the RC time constant of the above leaky capacitor. This is the dielectric relaxation time.
(b) Calculate the dielectric relaxation time $\varepsilon / \sigma$ of the following materials:
(i) A metal with $\sigma=10^{6}(\Omega \cdot \mathrm{~cm})^{-1}$ and $\varepsilon=10^{-13} \mathrm{C} / \mathrm{V} \cdot \mathrm{cm}$
(ii) An insulator with $\sigma=10^{-16}(\Omega \cdot \mathrm{~cm})^{-1}$ and $\varepsilon=3 \times 10^{-13} \mathrm{C} / \mathrm{V} \cdot \mathrm{cm}$
(iii) A semiconductor with $\sigma=10^{0}(\Omega \cdot \mathrm{~cm})^{-1}$ and $\varepsilon=10^{-12} \mathrm{C} / \mathrm{V} \cdot \mathrm{cm}$
5.8 The sample illustrated in Fig. P5.8 is illuminated on one end, a reflecting boundary, with light generating a sheet of electron-hole pairs at $x \approx 0$. The light has sufficient energy that all of the generated electrons are given so much energy that they are ejected from the semiconductor, where they are attracted to the positively biased electrode and appear as a current $i$ in the external circuit. (This process is called photoemission.)

The light generates $M$ hole-electron pairs $/ \mathrm{cm}^{2} \cdot \mathrm{~s}$ at $x=0$, and thus $i=q A M$, where $A$ is the cross-sectional area of the sample. $L=10 L_{h}$ and $D_{e}=3 D_{h}$.
(a) Sketch $p^{\prime}(x)$ for $0 \leq x \leq L$. Indicate the values of $p^{\prime}(x)$ at $x=0$ and at $x=L$.
(b) (i) Sketch the total current density $J_{\mathrm{TOT}}(x)$ for $0<x<L$.
(ii) Sketch the hole current density $J_{h}(x)$ for $0<x<L$. Indicate the values of $J_{h}(x)$ at $x=0^{+}$, that is, just to the right of the surface at $x=0$, and of $J_{h}(x)$ at $x=L^{-}$, that is, just before the ohmic contact at $x=L$.
(iii) Sketch the electron current density $J_{e}(x)$. Indicate the values of $J_{e}\left(0^{+}\right)$and $J_{e}\left(L^{-}\right)$.


FIGURE P5.8
5.9 Consider an open-circuited silicon bar $100 \mu \mathrm{~m}$ long with ohmic contacts on each end.

The bar is $p$-type with $N_{A}=5 \times 10^{16} \mathrm{~cm}^{-3}$; the electron mobility $\mu_{e}$ is $1600 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}$; the hole mobility $\mu_{h}$ is $600 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}$; and the minority carrier lifetime $\tau_{e}$ is $10^{-3} \mathrm{~s}$. The bar is illuminated with constant illumination generating $g_{L}(x)$ hole-electron pairs $/ \mathrm{cm}^{3} \cdot \mathrm{~s}$ in its bulk so that the resulting excess minority carrier concentration is as illustrated in Fig. P5.9.
(a) Calculate the minority carrier diffusion length for this sample, and justify the assumption of infinite lifetime. (See the discussion in Sec. 5.25 d .)
(b) Sketch and dimension the minority carrier current $J_{e}(x)$ for $0 \leq x \leq 100 \mu \mathrm{~m}$.
(c) Sketch and dimension the majority carrier current $J_{h}(x)$ for $0 \leq x \leq 100 \mu \mathrm{~m}$.
(d) Sketch and dimension the electric field $\mathscr{E}(x)$ for $0 \leq x \leq 100 \mu \mathrm{~m}$.
(e) What is the generation function $g_{L}(x)$ ? Sketch and dimension $g_{L}(x)$ for $0 \leq x \leq$ $100 \mu \mathrm{~m}$.


FIGURE P5.9


FIGURE P5.10
$(f)$ Sketch and dimension the net charge density $p(x)$ for $0 \leq x \leq 100 \mu \mathrm{~m}$. Compare your sketches of $\rho(x)$ and $g_{L}(x)$. They should look similar, which gives you a check on the consistency of your solution. (This is discussed in Sec. 5.2.6.)
(g) Thus far in this problem you have assumed no recombination in the bulk of this sample (i.e., infinite lifetime), but $\tau_{h}$ is not infinite, and recombination does occur.
(i) What is the total recombination flux density in the bulk of this sample in hole-electron pairs $/ \mathrm{cm}^{2} \cdot \mathrm{~s}$ ? [See Eq. (5.35) and the discussion preceding it.]
(ii) Compare this with the total rate at which hole-electron pairs are being generated (injected) in this sample by $g_{L}(x)$.
(iii) Where do the other hole-electron pairs go?
5.10 In this problem we want to compare the average velocities of drifting and diffusing charge carriers in the $p$-type silicon sample illustrated in Fig. P5.10. In this sample $N_{A}=1 \times 10^{17} \mathrm{~cm}^{-3}, \mu_{e}=1600 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}, \mu_{h}=600 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}, D_{e}=40 \mathrm{~cm}^{2} / \mathrm{s}$, $D_{h}=15 \mathrm{~cm}^{2} / \mathrm{s}$, and $\tau_{e}=10^{-6} \mathrm{~s}$.
(a) If we apply a voltage of 2 V to this sample, what are the electron and hole drift current densities and what are the average drift velocities of the electrons and holes?
b) Assume that the sample is illuminated with a narrow beam of light that generates hole-electron pairs in the plane at $x=5 \mu \mathrm{~m}$ and produces an excess electron population $n^{\prime}$ at $x=5 \mu \mathrm{~m}$ of $5 \times 10^{15} \mathrm{~cm}^{-3}$.
(i) What are the electron and hole diffusion current densities in the bar, and what are the average diffusion velocities of the electrons and holes at $x=1$ $\mu \mathrm{m}$ ?
(ii) What are the average drift velocities of the holes and electrons at $x=1$ $\mu \mathrm{m}$ ?
(c) At some point along the bar the average diffusing velocity of the minority carriers exceeds the thermal velocity, approximately $10^{7} \mathrm{~cm} / \mathrm{s}$, which is inconsistent with the assumptions made in developing the diffusing model and with what actually happens. In practice, the velocity of diffusion carriers saturates at about $10^{7} \mathrm{~cm} / \mathrm{s}$, and the velocity of drifting carriers saturates at about the same level.
(i) Find the regions in the bar in which the diffusion model is not valid for the minority carriers.
(ii) Is the diffusion model valid in these regions for the majority carriers? Why?
(iii) What happens to the electrons in these regions?

# NONUNIFORMLY DOPED SEMICONDUCTORS IN THERMAL EQUILIBRIUM 

Thus far we have considered only uniformly doped, homogeneous samples. We now want to consider samples in which the doping is a function of position. We restrict ourselves to one-dimensional variations, that is, $N_{d}(x)$ and $N_{a}(x)$, and begin by considering samples in thermal equilibrium. The question we will ask is, "Given $N_{d}(x)$ and $N_{a}(x)$, what are the thermal equilibrium hole and electron concentrations, $p_{o}(x)$ and $n_{o}(x)$, respectively, and what is the electric field $\mathscr{E}(x)$ ?" We do not ask about the electron and hole currents, $J_{e}$ and $J_{h}$, because in thermal equilibrium these currents are identically equal to zero and we need not be concerned any further with calculating them. In addition, we will show that it is still true in thermal equilibrium that $n_{o}(x) p_{o}(x)=n_{i}^{2}$ even if $n_{0}$ and $p_{o}$ are functions of position. Thus if we know $n_{0}(x)$, we know $p_{0}(x)$, and vice versa.

Before proceeding with answering the above question, we should consider why we even have a problem. Imagine that we have an $n$-type sample with $N_{D}(x)$ as illustrated in the Fig. 6.1. If we assume that $n_{0}(x) \approx N_{D}(x)$, then $n_{o}(x)$ would increase going from left to right and $p_{o}(x)$ would decrease. However, these gradients in $n_{0}$ and $p_{o}$ will cause the diffusion of electrons to the left and holes to the right, which in turn will lead to a charge imbalance and a negative electric field. This field will oppose the diffusion by tending to drift the holes to the left and electrons to the right (i.e., back to their original positions). A balance, or


FIGURE 6.1
Example of a net donor concentration $N_{D}(x)$, which varies with position.
equilibrium, is established in which the drift and diffusion fluxes just cancel each other. Clearly, however, we must anticipate that $n_{o}(x)$ will not equal $N_{D}(x)$, and that there will be an electric field.

### 6.1 GENERAL DESCRIPTION: THE POISSON-BOLTZMANN EQUATION

We begin by rewriting our five basic equations from Chap. 4:

$$
\begin{array}{r}
J_{e}(x, t)=q n(x, t) \mu_{e}(x) \mathscr{E}(x, t)+q D_{e}(x) \frac{\partial n(x, t)}{\partial x} \\
J_{h}(x, t)=q p(x, t) \mu_{h}(x) \mathscr{E}(x, t)-q D_{h}(x) \frac{\partial p(x, t)}{\partial x} \\
-\frac{1}{q} \frac{\partial J_{e}(x, t)}{\partial x}+\frac{\partial n(x, t)}{\partial t}=g_{L}(x, t)-r(T)\left[p(x, t) n(x, t)-n_{i}^{2}(T)\right] \\
\frac{1}{q} \frac{\partial J_{h}(x, t)}{\partial x}+\frac{\partial p(x, t)}{\partial t}=g_{L}(x, t)-r(T)\left[p(x, t) n(x, t)-n_{i}^{2}(T)\right] \\
\frac{\partial[\varepsilon(x) \mathscr{E}(x, t)]}{\partial x}=q\left[p(x, t)-n(x, t)+N_{d}(x)-N_{a}(x)\right] \tag{4.19}
\end{array}
$$

In the special circumstances that we are dealing with now (i.e., nonuniform doping and thermal equilibrium), there is no generation [i.e., $g_{L}(x, t)$ is zero]; the currents $J_{e}$ and $J_{h}$ are identically zero; and the carrier populations have their thermal equilibrium values. Furthermore, there is no time variation, so the time derivatives [in Eqs. (4.17) and (4.18)] are zero and all of the partial derivatives become total derivatives. In this case, Eqs. (4.17) and (4.18) reduce to $0=0$ and our five equations become three:

$$
\begin{equation*}
0=q n_{o}(x) \mu_{e}(x) \mathscr{E}(x)+q D_{e}(x) \frac{d n_{o}(x)}{d x} \tag{6.1a}
\end{equation*}
$$

$$
\begin{gather*}
0=q p_{o}(x) \mu_{h}(x) \mathscr{E}(x)-q D_{h}(x) \frac{d p_{o}(x)}{d x}  \tag{6.1b}\\
\frac{d[\varepsilon(x) \mathscr{E}(x)]}{d x}=q\left[p_{o}(x)-n_{o}(x)+N_{d}(x)-N_{a}(x)\right] \tag{6.1c}
\end{gather*}
$$

In spite of the enormous simplifications that these three equations represent compared to our initial five equations, they still form a set of coupled, nonlinear differential equations, and their solution is still difficult.

In order to proceed toward finding $p_{o}(x), n_{o}(x)$, and $\mathscr{E}(x)$ given $N_{d}(x)$ and $N_{a}(x)$ we start with Eq. (6.1a). Writing the electric field $\mathscr{E}(x)$, as $-d \phi / d x$, where $\phi(x)$ is the electrostatic potential, and rearranging terms yields

$$
\begin{equation*}
\frac{1}{n_{o}(x)} \frac{d n_{o}(x)}{d x}=\frac{\mu_{e}}{D_{e}} \frac{d \phi(x)}{d x} \tag{6.2}
\end{equation*}
$$

This equation can be integrated from a reference point to the position $x$ of interest. We obtain

$$
\begin{equation*}
\ln n_{o}(x)-\ln n_{\mathrm{ref}}=\frac{\mu_{e}\left[\phi(x)-\phi_{\mathrm{ref}}\right]}{D_{e}} \tag{6.3a}
\end{equation*}
$$

or, equivalently,

$$
\begin{equation*}
n_{o}(x)=n_{\mathrm{ref}} e^{\mu_{e}\left[\phi(x)-\phi_{\mathrm{ref}}\right] / D_{\varepsilon}} \tag{6.3b}
\end{equation*}
$$

where $\phi_{\text {ref }}$ is the electrostatic potential at some point that we will take as our reference position and $n_{\text {ref }}$ is the electron concentration at that same position.

It can be shown that the mobility $\mu$ and diffusion coefficient $D$ of a carrier are related through what is called the Einstein relation:

$$
\begin{equation*}
\frac{\mu_{e}}{D_{e}}=\frac{\mu_{h}}{D_{h}}=\frac{q}{k T} \tag{6.4}
\end{equation*}
$$

This relation occurs because both drift and diffusion involve carrier motion in gradients (of electrostatic potential energy and of concentration, respectively) and are dominated by the random thermal motion of carriers and collisions with the crystal lattice and defects. The Einstein relationship is easy to remember because it rhymes: "Mu over dee, is cue over kay tee." In fact, inverted it still rhymes: "Dee over mu, is kay tee over cue."

Using the Einstein relation, Eq. (6.3b) becomes

$$
\begin{equation*}
n_{o}(x)=n_{\mathrm{ref}} e^{q\left[\phi(x)-\phi_{\mathrm{ref}}\right] / k T} \tag{6.5}
\end{equation*}
$$

From the hole current equation we can obtain a similar expression for holes:

$$
\begin{equation*}
p_{o}(x)=p_{\mathrm{ref}} e^{-q\left\{\phi(x)-\phi_{\mathrm{ref}}\right\} / k T} \tag{6.6}
\end{equation*}
$$

We will take as our reference point intrinsic material. Thus $n_{\text {ref }}=n_{i}$ and $p_{\text {ref }}=n_{i}$. We will also take the zero reference for our potential to be intrinsic material (i.e., $\phi_{\text {ref }}=0$ ). We can do this as long as we are consistent and measure
all potentials relative to this zero reference. With this reference convention Eqs. (6.5) and (6.6) become

$$
\begin{equation*}
n_{o}(x)=n_{i} e^{q \phi(x) / k T} \tag{6.7}
\end{equation*}
$$

and

$$
\begin{equation*}
p_{o}(x)=n_{i} e^{-q \phi(x) / k T} \tag{6.8}
\end{equation*}
$$

The exponential factors in these equations are called Boltzmann factors. We can see that they take the form

$$
\begin{equation*}
e^{-\mathrm{PE} / \mathrm{TE}} \tag{6.9}
\end{equation*}
$$

where PE is the potential energy of the particle and TE is the thermal energy $k T$. The equations for $n_{o}(x)$ and $p_{o}(x)$ state that the ratio of the density, $n_{1}$ or $p_{1}$, of carriers with potential energy $\mathrm{PE}_{1}$, to the density, $n_{2}$ or $p_{2}$, of carriers with potential energy $\mathrm{PE}_{2}$ is a Boltzmann factor dependent on the difference between $\mathrm{PE}_{1}$ and $\mathrm{PE}_{2}$ :

$$
\begin{equation*}
\frac{n_{1}}{n_{2}}=\frac{p_{1}}{p_{2}}=e^{-\left(\mathrm{PE}_{1}-\mathrm{PE}_{2}\right) / k T}=e^{-\Delta \mathrm{PE} / k T} \tag{6.10}
\end{equation*}
$$

This type of behavior of a particle population at thermal equilibrium is found in a large number of physical systems. It is a feature we will make use of in a number of different device contexts.

Equations (6.7) and (6.8) give us two equations in three unknowns, $p_{o}(x)$, $n_{o}(x)$, and $\phi(x)$. Equation (6.1c), which is Poisson's equation, is the third equation. Assuming that the dielectric constant $\varepsilon$ does not vary with position and writing $\mathscr{E}(x)$ as $-d \phi / d x$, we have

$$
\begin{equation*}
\frac{d^{2} \phi(x)}{d x^{2}}=-\frac{q}{\varepsilon}\left[p_{o}(x)-n_{o}(x)+N_{D}(x)\right] \tag{6.11}
\end{equation*}
$$

where we have also used $N_{D}(x) \equiv N_{d}(x)-N_{a}(x)$ to denote the net donor concentration. Using Eqs. (6.7) and (6.8) in Eq. 6.11 gives us one equation in one unknown, $\phi(x)$ :

$$
\begin{equation*}
\frac{d^{2} \phi(x)}{d x^{2}}=-\frac{q}{\varepsilon}\left[n_{i}\left(e^{-q \phi(x) / k T}-e^{q \phi(x) / k T}\right)+N_{D}(x)\right] \tag{6.12a}
\end{equation*}
$$

or, equivalently,

$$
\begin{equation*}
\frac{d^{2} \phi(x)}{d x^{2}}=\frac{q}{\varepsilon}\left[2 n_{i} \sinh \frac{q \phi(x)}{k T}-N_{D}(x)\right] \tag{6.12b}
\end{equation*}
$$

This equation is called the Poisson-Boltzmann equation. It is a nonlinear, secondorder differential equation that is in general difficult to solve analytically. It can be readily solved by iteration using numerical methods, but it is still a solution best left for a computer. There are two special cases, however, in which approximate solutions can be found analytically: the first is when the doping varies gradually with position, and the second is an abrupt $p-n$ junction. We will discuss both of these in turn next.

### 6.2 GRADUAL SPATIAL VARIATION OF DOPING

If $N_{D}(x)$ [which is defined as $N_{d}(x)-N_{a}(x)$ ] is sufficiently slowly varying, then we can show that quasineutrality holds and that

$$
\begin{equation*}
n_{o}(x)-p_{o}(x) \approx N_{D}(x) \tag{6.13}
\end{equation*}
$$

If the material is extrinsic, $\left|N_{D}(x)\right| \gg n_{i}$, then for $n$-type materials we have

$$
\begin{align*}
& n_{n o}(x) \approx N_{D}(x)  \tag{6.14a}\\
& p_{n o}(x) \approx \frac{n_{i}^{2}}{N_{D}(x)} \tag{6.14b}
\end{align*}
$$

and

$$
\begin{equation*}
\phi_{n o}(x) \approx \frac{k T}{q} \ln \frac{N_{D}(x)}{n_{i}} \tag{6.14c}
\end{equation*}
$$

For $p$-type material, we have $N_{a}(x)$ greater than $N_{d}(x)$ and use $N_{A}(x)$ [defined as $\left.N_{a}(x)-N_{d}(x)\right]$ rather than $N_{D}(x)$. We find

$$
\begin{align*}
& p_{p o}(x) \approx N_{A}(x)  \tag{6.15a}\\
& n_{p o}(x) \approx \frac{n_{i}^{2}}{N_{A}(x)} \tag{6.15b}
\end{align*}
$$

and

$$
\begin{equation*}
\phi_{p o}(x) \approx-\frac{k T}{q} \ln \frac{N_{A}(x)}{n_{i}} \tag{6.15c}
\end{equation*}
$$

Notice that in writing Eqs. (6.14) and (6.15) we have introduced subscripts to indicate the net doping type (i.e., $n$ or $p$ ) of the regions in question.

When $N_{D}(x)$ is sufficiently slowly varying we thus know all of the answers; that is, we know $n_{o}(x), p_{o}(x)$, and $\phi_{o}(x)$. Quantitatively we can show that a "slow" variation of $N_{D}(x)$ means

$$
\begin{equation*}
\left|\frac{d \phi}{d x}\right| \ll \sqrt{\frac{k T\left|N_{D}\right|}{\varepsilon}} \tag{6.16}
\end{equation*}
$$

To see what this means physically, it is first useful to notice that the quantity on the right-hand side of this equation can be written in terms of the extrinsic Debye length, which we have defined [see Eq. (5.13) and App. D] as

$$
\begin{equation*}
L_{D}=\sqrt{D_{\mathrm{maj}} \tau_{D}} \tag{6.17}
\end{equation*}
$$

For the sake of discussion let us assume that we have a $p$-type sample so that $\tau_{D}=\varepsilon / q \mu_{h} p_{p o}$ and $D_{\text {maj }}=D_{h}=\mu_{h} k T / q$. Using these we can rewrite $L_{D}$ as

$$
\begin{equation*}
L_{D}=\sqrt{\frac{\varepsilon k T}{q^{2} p_{p o}}} \tag{6.18}
\end{equation*}
$$

Writing $L_{D}$ this way we see that Eq. (6.16) can also be stated as

$$
\begin{equation*}
\left|\frac{d \phi}{d x}\right| \ll \frac{k T}{q L_{D}} \tag{6.19}
\end{equation*}
$$

Now we can interpret this constraint more easily. It says that any change in the electrostatic potential of $k T / q$ must occur over many extrinsic Debye lengths $L_{D}$; alternatively, it says that over a distance of one extrinsic Debye length, the change in electrostatic potential must be much less than $k T / q$ for the quasineutrality condition to hold.

To cast these statements in terms of a variation in the doping concentration directly, assume that we have an $n$-type sample for which $N_{D}(x)$ is sufficiently slowly varying that $n_{n o}(x) \approx N_{D}(x)$. In this case we also have

$$
\begin{equation*}
\phi(x) \approx \frac{k T}{q} \ln \frac{N_{D}(x)}{n_{i}} \tag{6,20}
\end{equation*}
$$

and thus

$$
\begin{equation*}
\frac{d \phi}{d x} \approx \frac{k T}{q N_{D}(x)} \frac{d N_{D}}{d x} \tag{6.21}
\end{equation*}
$$

Inserting this into Eq. (6.19), we see that for our assumption of quasineutrality to hold, we must have

$$
\begin{equation*}
\left|\frac{d N_{D}}{d x}\right| \ll \frac{\left|N_{D}\right|}{L_{D}} \tag{6.22}
\end{equation*}
$$

where we have added absolute value signs to handle positive and negative doping gradients and net acceptor, as well as net donor, concentrations.

Thus far in this section, we have simply stated Eq. (6.16) and its other forms, Eqs. (6.19) and (6.22). To develop a feel for where these results come from we now look at an example in which we can obtain an approximate analytical solution. Consider a doping profile in which $N_{D}(x)=N_{o}$ for $x>0$ and $N_{D}(x)=N_{0}+\Delta N$ for $x<0$, where $\Delta N / N_{0}$ is small. This situation is illustrated in Fig. 6.2a.

For large $x$, that is, $x \gg 0$, we have $\phi(x)=\phi_{o}(k T / q) \ln \left(N_{o} / n_{i}\right)$. For any position we can write $\phi(x)$ as

$$
\begin{equation*}
\phi(x)=\phi_{0}+\Delta \phi(x) \tag{6.23}
\end{equation*}
$$

and we can write the Poisson-Boltzmann equation for $x>0$ as

$$
\frac{d^{2} \phi}{d x^{2}}=\frac{d^{2} \Delta \phi}{d x^{2}}=\frac{q}{\varepsilon}\left\{n_{i}\left[e^{-q\left(\phi_{0}+\Delta \phi\right) / k T}-e^{q\left(\phi_{0}+\Delta \phi\right) / k T}\right]-N_{o}\right\}
$$

Assuming that $|\Delta \phi| \ll k T / q$ and $N_{o} \gg n_{i}$, we find that this can be simplified to

$$
\begin{equation*}
\frac{d^{2} \Delta \phi}{d x^{2}} \approx \frac{q^{2} N_{o} \Delta \phi}{\varepsilon k T} \tag{6.24}
\end{equation*}
$$



FIGURE 6.2
(a) Doping profile with a step decrease in concentration at $x=0 ;(b)$ the corresponding $\phi(x)$.

From this we obtain the result that, for $x>0$,

$$
\begin{equation*}
\Delta \phi(x)=A e^{-x / L_{D}} \tag{6.25}
\end{equation*}
$$

with $L_{D} \equiv\left(\varepsilon k T / q^{2} N_{o}\right)^{1 / 2}$. Figure $6.2 b$ illustrates this function, which tells us that the carrier concentration will track the doping profile with a natural reaction distance of $L_{D}$. Our restriction, Eq. (6.19), follows directly.

We could continue with this solution, solving for $x<0$ and (by matching the two solutions at $x=0$ ) determining $A$, but the significance of the extrinsic Debye length should already be clear, and there is little to be gained by going further.

To summarize: if the variation in the doping profile $N(x)$ is gradual, then the equilibrium majority carrier population will be approximately $|N(x)|$. A "gradual" variation in doping implies a change in doping of no more than roughly 10 to 20 percent in one extrinsic Debye length $L_{D}$.

## $6.3 p-n$ JUNCTION: THE DEPLETION APPROXIMATION

A doping variation with tremendous practical importance is one in which the semiconductor type changes from $n$-type to $p$-type over a relatively short distance.

Such structures are called $p-n$ junctions, which form the heart of many electronic devices, as we shall learn.

### 6.3.1 Abrupt p-n Junction

An abrupt $p$ - $n$ junction is one in which the change from $n$ - to $p$-type occurs abruptly and in which the doping levels on either side of the junction are constant. This situation, illustrated in Fig. 6.3, can be represented mathematically by saying that $N_{D}(x)=-N_{A p}$ for $x<0$ and $N_{D}(x)=N_{D n}$ for $x \geq 0$.

To treat the problem of abrupt $p-n$ junctions we will use an approximation called the depletion approximation. This approximation, which can be used to treat junctions with many different doping profiles, has its foundations in the exponential variation of the equilibrium carrier concentrations with electrostatic potential, that is, Eqs. (6.7) and (6.8). This dependence implies that small changes in the potential $\phi$ will lead to very large changes in carrier concentrations, $n_{0}$ and $p_{o}$, and this fact can be exploited to our advantage.

In the $n$-type region, far from the junction, $n_{o}=N_{D n}, p_{0}=n_{i}^{2} / N_{D n}$, and $\phi=(k T / q) \ln \left(N_{D n} / n_{i}\right)$. In the $p$-type region, far from the junction, $p_{o}=N_{A p}$, $n_{o}=n_{1}^{2} / N_{A p}$ and $\phi=-(k T / q) \ln \left(N_{A p} / n_{i}\right)$. The electrostatic potential on the $n$-side is written as $\phi_{n}$ and on the $p$-side as $\phi_{p}$, and we have

$$
\begin{equation*}
\phi_{n}=\left(\frac{k T}{q}\right) \ln \frac{N_{D n}}{n_{i}} \tag{6.26a}
\end{equation*}
$$

and

$$
\begin{equation*}
\phi_{p}=-\left(\frac{k T}{q}\right) \ln \frac{N_{A p}}{n_{i}} \tag{6.26b}
\end{equation*}
$$

Example
Question. What is the value of the electrostatic potential, referenced to intrinsic material, in each of the following silicon samples at room temperature: a) $N_{D n}=$


FIGURE 6.3
Doping profile at an abrupt $p-n$ junction.
$2.5 \times 10^{15} \mathrm{~cm}^{-3}$; b) $N_{D n}=2 \times 10^{17} \mathrm{~cm}^{-3}$; and c) $N_{A p}=4 \times 10^{16} \mathrm{~cm}^{-3} ?$ Assume that $n_{i}$ is $1 \times 10^{10} \mathrm{~cm}^{-3}$ and $k T / q$ is 0.025 V .

Discussion. Using Eqs. (6.26) we find that $\phi$ is 0.31 V in sample a, and 0.42 V in sample b , and -0.38 V in sample c . We see that although the doping levels differ by almost two orders of magnitude, the magnitudes of the electrostatic potentials are all very comparable; this reflects the fact that the electrostatic potential depends only logarithmically on the doping level.

Crossing from the $n$-region to the $p$-region, $n_{o}$ changes many orders of magnitude and the associated gradient in concentration leads to a diffusion flux of electrons from the $n$-side to the $p$-side of the junction. The complementary change in $p_{o}$ leads to an oppositely directed diffusion of holes. These diffusion currents will be counterbalanced by drift currents because the motion of negatively charged electrons in one direction and positively charged holes in the other causes a polarization, or charge imbalance, that creates an electric drift field that opposes further motion. An equilibrium situation develops in which the drift and diffusion currents exactly cancel and the net hole and electron currents are identically zero, as we have discussed before.

The electric field, of course, reflects the fact that $\phi$ changes from $\phi_{n}$ to $\phi_{p}$ going across the junction. As $\phi(x)$ decreases from $\phi_{n}$ as the junction is approached, it must be true that $n_{o}(x)$ decreases even more quickly from $N_{D_{n}}$ (because it depends exponentially on $\phi$ ). This is illustrated in Fig. 6.4. Any decrease in $n_{o}(\mathrm{x})$ below $N_{D n}$, leaves a net, fixed positive charge density $\rho(x) \approx q\left[N_{D n}-n_{o}(x)\right]$ at that position. This is illustrated in Fig. 6.4. The hole population $p_{o}(x)$ is increasing exponentially at the same time that $n_{o}(x)$ is decreasing, but until $\phi(x)$ becomes very negative (approximately $-\phi_{n}$ ) the amount of charge due to the mobile holes is negligible. Thus when the change in $\phi$ is


FIGURE 6.4
Comparison of changes in (a) electrostatic potential, versus (b) equilibrium electron population. (The values at $x=0$ correspond to silicon at room temperature with $N_{D n}=10^{16} \mathrm{~cm}^{-3}$.)
more than a few $k T / q, n_{o}(x)$ will be much smaller than $N_{D n}$ and the net charge density $\rho(x)$ will be essentially $q N_{D n}$.

Similarly, on the $p$-side, as $\phi(x)$ increases from $\phi_{p}, p_{0}(x)$ decreases quickly, and after an increase of only a few $k T / q$ in $\phi, p_{o}(x)$ is much less than $N_{A p}$ and we have $\rho(x) \approx-q N_{A p}$.

The total change in potential, $\phi_{n}-\phi_{p}$, is many $k T / q$, so we might anticipate that these initial changes of only a few $k T / q$ will occur over only a small fraction of the total distance over which the total change in $\phi$ occurs. In the depletion approximation we assume that the changes illustrated in Fig. 6.4 occur over negligibly short distances and thus that the change from $\rho(x)=0$ to $\rho(x)=q N_{D n}$ on the $n$-side occurs abruptly at some $x \equiv x_{n}$. Similarly we say that $\rho(x)$ changes abruptly from 0 to $-q N_{A p}$ at $x \equiv-x_{p}$ on the $p$-side. Between $x=-x_{p}$ and $x=x_{n}$, both $n_{0}(x)$ and $p_{o}(x)$ are assumed to be negligibly small compared to the fixed donor and acceptor densities, $N_{A p}$ and $N_{D n}$. This is illustrated in Fig. 6.5a. Having an estimate of the net charge density $\rho(x)$, we can proceed to solve Eq. (6.11) for the electrostatic potential.

Formally, in the depletion approximation we assume that the charge density has the following positional dependence:

$$
\rho(x)=\left\{\begin{array}{ccr}
0 & \text { for } & x<-x_{p}  \tag{6.27}\\
-q N_{A p} & \text { for } & -x_{p}<x<0 \\
+q N_{D n} & \text { for } & 0<x<x_{n} \\
0 & \text { for } & x_{n}<x
\end{array}\right.
$$

The positions $x_{p}$ and $x_{n}$ are unknown at this point in our discussion, but we will obtain expressions for them shortly. We will get one relationship between $x_{p}$ and $x_{n}$ by insisting that the total change in the potential must be equal to $\phi_{n}-\phi_{p}$. We can get another relationship by noticing that the total charge in the system must be conserved and that the net charge must be zero. Thus it must be true that

$$
q N_{A p} x_{p}=q N_{D n} x_{n}
$$

so we can write

$$
\begin{equation*}
\frac{x_{n}}{x_{p}}=\frac{N_{A p}}{N_{D n}} \tag{6.28}
\end{equation*}
$$

Having specified $\rho(x)$, we next obtain the electric field $\mathscr{E}(x)$ by integrating the charge density once. We find

$$
\mathscr{E}(x)=\left\{\begin{array}{ccr}
0 & \text { for } & x<-x_{p}  \tag{6.29}\\
-q N_{A p}\left(x+x_{p}\right) / \varepsilon & \text { for } & -x_{p}<x<0 \\
q N_{D n}\left(x-x_{n}\right) / \varepsilon & \text { for } & 0<x<x_{n} \\
0 & \text { for } & x_{n}<x
\end{array}\right.
$$

In arriving at this result, we have used the boundary condition that there is no electric field far away from the junction on either side of the space charge region. This electric field is plotted in Fig. 6.5b.


FIGURE 6.5
Depletion approximation solution in the vicinity of an abrupt $p-n$ junction for: (a) the net charge density; (b) the electric field; (c) the electrostatic potential; and (d) the mobile charge populations.

Next, a second integration gives us $\phi(x)$ :

$$
\phi(x)=\left\{\begin{array}{ccr}
\phi_{p} & \text { for } & x<-x_{p}  \tag{6.30}\\
\phi_{p}+q N_{A p}\left(x+x_{p}\right)^{2} / 2 \varepsilon & \text { for } & -x_{p}<x<0 \\
\phi_{n}-q N_{D n}\left(x-x_{n}\right)^{2} / 2 \varepsilon & \text { for } & 0<x<x_{n} \\
\phi_{n} & \text { for } & x_{n}<x
\end{array}\right.
$$

This result is plotted in Fig. 6.5c.
We obtain our second relationship between $x_{n}$ and $x_{p}$ by matching the expressions for $\phi(x)$ at $x=0$. Doing this and using Eq. (6.28), we arrive at

$$
\begin{align*}
& x_{n}=\sqrt{\frac{2 \varepsilon \phi_{b}}{q} \frac{N_{A p}}{N_{D n}\left(N_{A p}+N_{D n}\right)}}  \tag{6.31a}\\
& x_{p}=\sqrt{\frac{2 \varepsilon \phi_{b}}{q} \frac{N_{D n}}{N_{A p}\left(N_{A p}+N_{D n}\right)}} \tag{6.31b}
\end{align*}
$$

In writing these equations we have introduced the quantity $\phi_{b}$, which we call the built-in potential and define as $\phi_{n}-\phi_{p}$, the total change in potential seen in traversing the junction. Using Eqs. (6.26) we see that the built-in potential can be written as

$$
\begin{equation*}
\phi_{b}=\frac{k T}{q} \ln \left(\frac{N_{D n} N_{A p}}{n_{i}^{2}}\right) \tag{6.32}
\end{equation*}
$$

The total depletion region width $w$ is given by

$$
\begin{equation*}
w \equiv x_{n}+x_{p}=\sqrt{\frac{2 \varepsilon \phi_{b}}{q} \frac{N_{A p}+N_{D n}}{N_{A p} N_{D n}}} \tag{6.33}
\end{equation*}
$$

The peak electric field in the junction, which occurs at $x=0$, is given by

$$
\begin{equation*}
\mathscr{E}_{\mathrm{pk}}=\mathscr{C}(0)=-\sqrt{\frac{2 q \phi_{b}}{\varepsilon}} \sqrt{\frac{N_{A p} N_{D n}}{N_{A p}+N_{\mathrm{Dn}}}} \tag{6.34}
\end{equation*}
$$

## Example

Question. Consider two silicon $p-n$ junctions, the first in which the $p$-side doping $N_{A p}$ is $4 \times 10^{16} \mathrm{~cm}^{-3}$ and the $n$-side doping $N_{D n}$ is $2.5 \times 10^{15} \mathrm{~cm}^{-3}$, and the second in which $N_{A p}$ is $4 \times 10^{16} \mathrm{~cm}^{-3}$ and $N_{D n}$ is $2 \times 10^{17} \mathrm{~cm}^{-3}$. What are the built-in potentials, what are the widths of the depletion regions, what fraction of this width is on the $n$-side of the junction, and what are the peak electric fields in each of these two junctions?

Discussion. Substituting the appropriate values into Eq. (6.32) for the built-in potential we calculate that $\phi_{b}$ is 0.69 V in the first junction and 0.80 V in the second. These two values are comparable even though the doping levels on the $n$-sides of the junctions differ by a factor of 80 . This reflects the fact that the built-in potential depends only logarithmically on the doping levels.

Using Eq. (6.33) for the depletion region width we calculate that $w$ is 0.6 $\mu \mathrm{m}(600 \mathrm{~nm})$ in the first junction and $0.17 \mu \mathrm{~m}(170 \mathrm{~nm})$ in the second. We see that the width is greater in the more lightly doped junction (i.e., the first junction). This is true in general and is an important observation.

In the first junction the depletion region on the $n$-side is 16 times as wide as that on the $p$-side, since, as we know from Eq. (6.28), the widths vary inversely with the doping levels. Thus 94 percent of the depletion occurs in the $n$-region, which is the more lightly doped side of this junction. In the second junction, in which the $n$-side of the junction is the more heavily doped, the depletion region on the $n$-side is the smaller of the two depletion regions, being one-fifth as large as that on the $p$-side. The observation that the depletion region extends primarily into the more lightly doped side of a junction has important implications and applications. We will encounter it in several device situations.

Finally, using Eq. (6.34) to calculate the peak electric field in each of the two junctions, we find that it is $2.2 \times 10^{4} \mathrm{~V} / \mathrm{cm}$ in the first and $8.8 \times 10^{4} \mathrm{~V} / \mathrm{cm}$ in the second. That the electric field is higher in the more heavily doped junction is another general observation that must be taken into consideration in device design.

The solution of the depletion approximation is now complete in that we have an expression for $\phi(x)$. This is only an approximate solution, however. Notice that it is not a self-consistent solution. If we use our approximate $\phi(x)$ to calculate $n_{o}(x)$ and $p_{o}(x)$ using the Boltzmann factor expressions, Eqs. (6.7) and (6.8), we get the results shown in Fig. 6.5d. If we then calculate $\rho(x)$, we find that it is not the same as we originally assumed, that is, according to Eq. (6.27). In particular, $\rho(x)$ does not change from 0 to $q N_{A p}$ abruptly at $x=-x_{p}$, nor does it change abruptly at $x=x_{n}$, as we of course know it must not. But it does change quickly, changing by a factor of 100 within about three extrinsic Debye lengths. If we wish to improve the solution (and the self-consistency) we could use the "new" $\rho(x)$ as the starting point for a second solution for $\phi(x)$, integrating $\rho(x)$ twice as we did with our first $\rho(x)$. This iteration process could be continued as long as we wished, that is, until the solution converged to within acceptable limits (set by us) to the "true" solution, as evidenced by how little it changed between successive iterations. Because of the exponential dependence of $n_{o}$ and $p_{o}$ on $\phi$ and because the two integrations have a strong smoothing effect, this iterative process converges very quickly. This is one common method of solving the Poisson-Boltzmann equation numerically.

In Fig. 6.6 more accurate solutions obtained by such an iterative technique are compared with the depletion approximation. Certainly in terms of the quantities of interest, the peak electric field and the depletion region width, the depletion approximation is very good and is an extremely useful model.

## Example

Question. For the junctions considered in the previous example, what are the extrinsic Debye lengths on the $n$ - and $p$-sides of the junctions and how do they compare with $x_{n}$ and $x_{p}$, respectively?

Discussion. The extrinsic Debye lengths are $40 \mathrm{~nm}, 10 \mathrm{~nm}$, and 4.5 nm , respectively, in the regions doped to $2.5 \times 10^{15} \mathrm{~cm}^{-3}, 4 \times 10^{16} \mathrm{~cm}^{-3}$, and $2 \times 10^{17} \mathrm{~cm}^{-3}$. In the first diode the depletion width on the $p$-side of the junction is 35 nm and on the $n$-side is 565 nm . The corresponding extrinsic Debye lengths are 10 and 80 nm , respectively. We can see that the depletion region width is only 7 extrinsic Debye lengths on the $p$-side, whereas it is more than 10 on the $n$-side , Nonetheless, the


FIGURE 6.6
Comparison of accurate solutions in the vicinity of an abrupt $p-n$ junction with the results of the depletion approximation: $(a) \rho(x) ;(b) \mathscr{E}(x) ;(c) \phi(x)$; (d) $n_{o}(x)$ and $p_{o}(x)$. (Dashed lines represent the approximation.)
depletion approximation is a good model even on the $p$-side. In the second diode the depletion width on the $p$-side of the junction is 140 nm , whereas the extrinsic Debye length is 10 nm ; and on the $n$-side $x_{n}$ is 28 nm and $L_{D e}$ is 2.5 nm . The depletion approximation can be expected to be very good for this junction.

### 6.3.2 Other $p$ - $n$ Junction Profiles

The abrupt $p-n$ junction is only one of many possible doping profiles encountered in practical situations. Strictly speaking, a perfectly abrupt junction is never found in practice because the change from $p$ - to $n$-type doping always occurs over a finite distance, depending on the fabrication technique used to produce the junction. If the distance is much less than the depletion region width $w$, however, and the regions outside the transition are uniformly doped, then the assumption that the junction is abrupt will still be a good one. If the change is somewhat more gradual but still narrower than $w$, the depletion approximation can still be applied, as long as the true $N_{D}(x)$ is used.

In fact, the depletion approximation can be applied to any junction profile for which $N_{D}(x)$ is "slowly varying" (as described earlier) at the edges of the depletion region. The only difficulty may be in obtaining a closed-form solution because the change in potential in crossing the junction will depend on the doping levels at the edges of the depletion region. A certain amount of additional iteration is required.

A useful nonabrupt doping profile is the linearly graded junction, that is, one in which $N_{D}(x)$ can be expressed as

$$
\begin{equation*}
N_{D}(x)=a x \tag{6.35}
\end{equation*}
$$

where the grading constant $a$ has units of $\mathrm{cm}^{-4}$. This profile is illustrated in Fig. $6.7(a)$. Another common profile is the exponentially graded junction:

(a)

(b)

FIGURE 6.7
Two commonly encountered junction profiles: (a) linearly graded; (b) exponentially graded.

$$
\begin{equation*}
N_{D}(x)=N\left[e^{\left(x-x_{j}\right) / L}-1\right] \tag{6.36}
\end{equation*}
$$

where $x_{j}$ is the position of the junction and $L$ is the dimension describing the specific profile under study. This profile, with $x_{j}=0$, is illustrated in Fig. 6.7b.

### 6.4 THE ELECTROSTATIC POTENTIAL AROUND A CIRCUIT

A reasonable question to ask upon looking at Fig. $6.5 c$ is whether the potential change of $\phi_{b}$ going from the $p$-side to the $n$-side of a $p$ - $n$ junction can be measured with a voltmeter at the diode terminals and possibly even be used as a battery. The answer is no, but understanding why requires a bit of explanation and is worth considering before the next chapter, where we will be applying an external bias to such diodes.

To measure the voltage across a junction requires that we apply contacts to the end of the device. In the process, we form several other junctions including those between the contact metal or metals and the $n$ - and $p$-type semiconductor, and possibly between several semiconductor regions with different doping levels. A possible example is illustrated in Fig. 6.8a. In this figure we assume that the contact metal and wires are all aluminum. We have also added heavily doped $n$ and $p$-regions on either end of the diode to facilitate making good ohmic contacts.

We can calculate the electrostatic potential relative to intrinsic silicon in each of the variously doped regions of the semiconductor bar in Fig. 6.8 using Eqs. (6.26). The electrostatic potential of aluminum relative to intrinsic silicon is approximately -0.3 V . If we now plot the potential, moving from one lead and contact into the heavily $p$-type region and on through the device to the other contact and lead, we find that the potential decreases at some junctions and increases at others, as is illustrated in Fig. $6.8 b$. The net change in potential, however, is zero. Thus no voltage is measured between the terminals and no current flows when the two leads are shorted together, as they are in Fig. 6.8a. We know this must be the case if we are in thermal equilibrium because a nonzero current would imply that there is a net flow of energy, which is clearly not an equilibrium situation.

At each junction in the circuit a dipole layer forms, just as it did at the $p-n$ junction where a relatively wide depletion region formed. At points where the potential steps are small, and between two similarly doped regions (i.e., $n$ to $n^{+}$or $p$ to $p^{+}$), the dipole layer is very thin and will be of little consequence to us when we study current flow in Chap. 7. Between the aluminum and the $n$-silicon, however, the potential step is large and could introduce a significant barrier, but again the depletion region can be made very narrow and the junction inconsequential by heavily doping the silicon next to the metal. This is part of the science of making good ohmic contacts; such technology is not our concern here, but it is discussed in Apps. E and G. It will be sufficient in Chap. 7 for us to say that we can build diodes in which the only junction that "matters" as far as the external bias and current flow are concerned is the main $p-n$ junction. For purposes of our thermal equilibrium discussion in this chapter, however, it


FIGURE 6.8
(a) Typical abrupt $p-n$ diode with two aluminum ohmic contacts and an aluminum wire connecting them; (b) plot of the electrostatic potential through the structure in (a); (c) the corresponding net charge distribution.
does not even matter whether the dipole layers are thick or thin. In either event the total potential step crossing each junction is the difference in the electrostatic potentials on either side, and thus the total potential charge in going around a circuit is identically zero.

Consider what would happen if one of the leads on the device in Fig. $6.8 a$ were copper. As soon as you complete the circuit-whether by touching the copper and aluminum leads or by shorting them together with yet a third metal, say silver-small dipole layers develop at each new junction and the appropriate
potential steps develop. The total potential drop going around the circuit is still zero and no current flows. This must, of course, always be the case because we are in thermal equilibrium.

### 6.5 SUMMARY

In this chapter we have first shown that in the case of an arbitrarily doped semiconductor in thermal equilibrium, our five basic equations describing semiconductors reduce to a single second-order differential equation for the electrostatic potential; we call this equation the Poisson-Boltzmann equation. Knowing the electrostatic potential $\phi(x)$, we can immediately determine the equilibrium hole and electron concentrations, $p_{o}(x)$ and $n_{o}(x)$ :

$$
\begin{gathered}
n_{o}(x)=n_{i} e^{q \phi(x) / k T} \\
p_{o}(x)=n_{i} e^{-q \phi(x) / k T}
\end{gathered}
$$

We can also readily calculate the electric field $\mathscr{E}$ :

$$
\mathscr{E}(x)=-\frac{d \phi(x)}{d x}
$$

(In thermal equilibrium there are no currents.)
We have considered two common special cases of nonuniform doping. The first was that in which the doping changes gradually in magnitude, but not type, with position, and we found that in this case the majority carrier population tracks the net doping concentration profile. The second case was an abrupt $p-n$ junction, for which we found that we could use a model called the depletion approximation to estimate the depletion region width and the electric field in the depletion region (also called the space charge layer). In the depletion approximation model, we assume that the mobile hole and electron populations are identically zero within the depletion region and have their equilibrium values elsewhere. This gives an estimate for the net charge distribution, which we can then integrate twice to get the electrostatic potential. Fitting the result to the known potential change across the junction, which we call the built-in potential, gives us the depletion region widths on the $n$ - and $p$-sides of the junction.

Having developed our model, we observed that the depletion region extends predominantly into the more lightly doped side of a junction and also that the depletion region is wider in more lightly doped junctions and relatively narrower in heavily doped junctions. We have also seen that the peak electric field in the depletion region is greater in more heavily doped junctions. These are all important observations that we will use when designing junction devices such as diodes and bipolar transistors.

Finally, we have discussed the electrostatic potential change experienced crossing a $p-n$ junction and asked whether it represents a possible source of energy. We argued that as we add leads to our device and complete the circuit through which this energy would flow, we find that there are, in fact, potential steps, some up and some down, at each interface or junction between different materials in the circuit. We saw that the net result is that the change in potential
going around a circuit in thermal equilibrium is zero and that a $p-n$ junction in thermal equilibrium is not a battery.

## PROBLEMS

6.1 This problem provides practice with basic relationships.
(a) Find the electrostatic potential $\phi$ in the following samples, assuming $\phi$ is zero in intrinsic material:
(i) $n$-type Si, $n_{0}=5 \times 10^{17} \mathrm{~cm}^{-3}$
(ii) $p$-type Si, $p_{o}=1 \times 10^{18} \mathrm{~cm}^{-3}$
(iii) $p$-type $\mathrm{Si}, p_{o}=1 \times 10^{16} \mathrm{~cm}^{-3}$
(iv) $p$-type Ge, $p_{o}=1 \times 10^{16} \mathrm{~cm}^{-3}$
(b) Find the carrier diffusion coefficient or mobility as indicated in each of the following samples at room temperature ( $300 \mathrm{~K}, k T / q \approx 0.025 \mathrm{~V}$ ):
(i) Si: $\mu_{e}=1500 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}, D_{e}=$ ?
(ii) Si: $D_{e}=30 \mathrm{~cm}^{2} / \mathrm{s}, \mu_{e}=$ ?
(iii) GaP: $D_{e}=30 \mathrm{~cm}^{2} / \mathrm{s}, \mu_{e}=$ ?
(iv) Ge: $\mu_{h}=2000 \mathrm{~cm}^{2} / \mathrm{s}, D_{h}=$ ?
(c) Repeat b at $125^{\circ} \mathrm{C}$ (approximately 400 K ).
6.2 In this problem we will be concerned with three different silicon samples: an $n$-sample with $N_{n}=5 \times 10^{15} \mathrm{~cm}^{-3}$, an $n^{+}$-sample with $N_{n}=10^{18} \mathrm{~cm}^{-3}$, and a $p$-sample with $N_{p}=10^{17} \mathrm{~cm}^{-3}$. (Note: By writing $n^{+}$we denote a heavily doped $n$-type sample.)
(a) Following our convention that $\phi=0$ in intrinsic material, what is $\phi$ in each of these samples at room temperature?
(b) Calculate the built-in voltage $\phi_{b}$ of a junction (i) between the $p$ - and $n$-samples and (ii) between the $p$ - and $n^{+}$-samples.
(c) Derive an expression for the electrostatic potential difference between two uniformly doped $n$-type regions. Use this expression to calculate the potential difference (built-in potential) between the $n$ - and $n^{+}$-samples.
(d) The electrostatic potential of a certain metal relative to intrinsic silicon is -0.05 V at room temperature. What is the contact potential between this metal and (i) the $n^{+}$-sample? (ii) the $p$-sample?
(e) Use your answers from parts a through d to show that the change in electrostatic potential going around the circuit shown in Fig. P6.2 is zero.
6.3 Calculate the depletion region width in the following junctions. In each case compare your answer to the extrinsic Debye length on the more lightly doped side of the


FIGURE P6.2
junction. Refer to Table A. 1 of App. A as needed.
(a) Silicon: $N_{D n}=10^{17} \mathrm{~cm}^{-3}, N_{A p}=5 \times 10^{15} \mathrm{~cm}^{-3}$
(b) Silicon: $N_{D n}=10^{17} \mathrm{~cm}^{-3}, N_{A p}=5 \times 10^{18} \mathrm{~cm}^{-3}$
(c) Germanium: $N_{D n}=10^{15} \mathrm{~cm}^{-3}, N_{A p}=5 \times 10^{16} \mathrm{~cm}^{-3}$
(d) Gallium arsenide: $N_{D n}=10^{17} \mathrm{~cm}^{-3}, N_{A p}=5 \times 10^{18} \mathrm{~cm}^{-3}$
6.4 A linearly graded junction is an approximation to the doping profile created by the diffusion of impurities into a semiconductor to form a deep $p-n$ junction. It is described by the relationship

$$
N(x)=N_{d}(x)-N_{a}(x)=a x
$$

where $a$ has the units of $\mathrm{cm}^{-4}$ and is called the grading constant.
(a) Use the depletion approximation to calculate expressions for and make rough sketches of the following quantities when $v_{A}=0$, assuming that the depletion region width $w$ is known:
(i) Net charge density $\rho(x)$ for $-w<x<w$
(ii) Electric field $\mathscr{E}(x)$ for $-w<x<w$
(iii) Electrostatic potential $\phi(x)$ for $-w<x<w$
(b) Derive two expressions for the built-in potential $\phi_{b}=\phi(w / 2)-\phi(-w / 2)$ as follows:
(i) Based on your expression in part (iii) above
(ii) Based on knowing $p_{1}(-w / 2)$ and $n_{1}(w / 2)$ and using the Boltzmann relations ( $n=n_{i} e^{q \phi / k T}$, etc.)
(c) Setting equal the two expressions you found in b for $\phi_{b}$ equal yields a transcendental equation that would have to be solved to find $w$. Write out this equation and find $\phi_{b}$ and $w$ when $a$ is $10^{20} \mathrm{~cm}^{-4}$.
6.5 A useful variant on the abrupt $p-n$ junction is the $p-i-n$ diode, where $i$ stands for intrinsic. An example is pictured in Fig. P6.5. The idea of this structure is that the largest electric fields and most of the voltage drop occurs across the intrinsic region. In this problem use $w_{n}=w_{p}=2 \mu \mathrm{~m}$ and $w_{i}=1 \mu \mathrm{~m}$. Also assume that $T=27^{\circ} \mathrm{C}$ ( 300 K ) and that $n_{i}=10^{10} \mathrm{~cm}^{-3}$.
(a) What is the electrostatic potential on the $n$ - and $p$-sides of this diode far from the interfaces (i.e., in the quasineutral regions)?
(b) What are both $n_{o}$ and $p_{o}$ in each of the two quasineutral regions?
(c) Sketch and dimension $N(x)$, the net donor concentration as a function of $x$, for $-w_{p}<x<w_{i}+w_{n}$.
(d) Assuming depletion regions of width $x_{p}$ and $x_{n}$ on the $p$ - and $n$-sides of the junction, respectively, what is the ratio of $x_{n}$ to $x_{p}$ ?


FIGURE P6.5


FIGURE P6. 6
(e) Sketch and dimension the net charge distribution $\rho(x)$ as a function of $x$ for $-w_{p}<x<w_{i}+w_{n}$, assuming that the depletion approximation is a good model. Do not solve for $x_{n}$ and $x_{p}$, but assume that they are known and are smaller than $w_{i}$
(f) Sketch and dimension the electric field profile $\mathscr{E}(x)$ for $-w_{p}<x<w_{i}+w_{n}$ using the depletion approximation. Assume that $x_{n}$ and $x_{p}$ are known and are smaller than $w_{i}$
(g) Estimate a realistic lower bound for the approximate applied voltage that would result in a peak electric field of $10^{5} \mathrm{~V} / \mathrm{cm}$ in this device. Think about this question a bit; you should not have to solve for $x_{n}$ and $x_{p}$ in order to answer.
6.6 Consider a silicon diode with the doping profile illustrated in Fig. P6.6.
(a) Sketch and label the net charge distribution $\rho(x)$ in this structure, assuming that the depletion approximation is valid.
(b) Sketch and label the electric field profile $\mathscr{E}(x)$ throughout this structure.
(c) Sketch and label the electrostatic potential $\phi(x)$ in this structure.
(d) Calculate the zero bias depletion region width in this structure.
6.7 Find the electric field and electrotatic potential profile due to the charge distribution shown in Fig. P6.7. Make labeled sketches of $\mathscr{E}(x)$ and the potential $\phi(x)$. In your potential plot take the reference potential to be $\phi=0$ at $x=0$.


FIGURE P6.7


FIGURE P6.8
6.8 The $p-n$ junction shown in Fig. P6.8 has an impulse of doping, $\sigma$, at the origin. The width of the space charge layer on the $p$-side is $x_{p}$ and on the $n$-side is $x_{n}$.
(a) Find an expression that relates $x_{n}$ to $x_{p}$.
(b)(i) Make a labeled plot of $\mathscr{E}(x)$. Label in terms of $N, \sigma, x_{p}$ and $\mathscr{E}$.
(ii) Do the same for $\phi(x)$.
(c) Write an equation for $x_{p}$ (in terms of $q, N, \sigma, \mathscr{E}$, and $\phi_{b}$ ) that you can use to solve for the value of $x_{p}$.

## CHAPTER 7

## JUNCTION DIODES

The $p-n$ junction diode is a very important device that we are now in a position to understand. We have just discussed modeling a $p-n$ junction in thermal equilibrium, and the next logical step is to force our junction out of equilibrium. We will do this by applying a voltage, illumination, or both to it, and we will then see what happens. As we shall see shortly, some extremely useful things happen, and we will be able to do a great deal even with a single $p-n$ junction.

### 7.1 APPLYING VOLTAGE TO A $p \cdot n$ JUNCTION

In Sec. 6.4 we considered the changes in the electrostatic potential as we went around a circuit through a short-circuited abrupt $p$ - $n$ diode and found that although there were steps up and down, the net change in potential was zero, as we knew it had to be. Now consider breaking the circuit by parting the wire connecting the two ohmic contacts, which we label A and B , and applying an external voltage source that will create a potential difference $v_{A B}$ between the two contacts. This is illustrated in Fig. 7.1a.

In our model for a $p-n$ diode, we will assume that the only effect of introducing $\nu_{\mathrm{AB}}$ on the electrostatic potential picture of Fig. 6.5 c is to change the potential step in crossing the junction from $\phi_{b}$ to $\phi_{b}-v_{A B}$. None of the other potential steps change.

This assumption, in effect, says that none of the other parts of the diode structure present a significant impediment to current flow and equilibrium; only the abrupt $p-n$ junction plays a major role, and it somehow (as we shall describe shortly) "absorbs" the deviation from equilibrium (i.e., the effects of the nonequilibrium external voltage source excitation).


FIGURE 7.1
(a) The diode of Fig. $6.8 a$ with an external voltage applied to the terminals; (b) the possible contributions to the effective nonlinear resistance of a $p-n$ diode like that in Fig. 7.1a; (c) the variation in the electrostatic potential through the structure with a negative applied bias (i.e., $v_{A B}<0$ ).

A simple picture may help you understand. Figure $7.1 b$ shows schematically the various pieces in the diode circuit that might impede current flow and thus absorb some of the applied voltage. We picture these pieces as resistors, recognizing that this may be very crude given that there is no a priori reason to expect all of these regions to show ohmic behavior (i.e., a linear relationship between voltage and current). Beginning with the left-most contact, we have first the interface between the metal and the $p^{+}$-silicon $\left(R_{1}\right)$, then the resistance of the $p^{+}$-region $\left(R_{2}\right)$, the $p^{+}-p$ junction $\left(R_{3}\right)$, the resistance of the $p$-region up to the edge of the space charge region $\left(R_{4}\right)$, the $p-n$ junction proper $\left(R_{5}\right)$, the resistance of the $n$-region $\left(R_{6}\right)$, the $n-n^{+}$junction $\left(R_{7}\right)$, the resistance of the $n^{+}$-region $\left(R_{8}\right)$, the $n^{+}$-region-to-metal contact ( $R_{9}$ ), and finally the resistance of the wire ( $R_{10}$ ). Some of these resistances ( $R_{2}, R_{4}, R_{6}$, and $R_{8}$ ) can clearly be made low by suitably doping the semiconductor and others ( $R_{10}$ ) by using good wire.

The contact resistances ( $R_{1}$ and $R_{9}$ ) and the $p^{+}-p$ and $n-n^{+}$resistances ( $R_{3}$ and $R_{7}$ ) are less familiar to you. Referring to Fig.7.1c and looking first at the $p-p^{+}$and $n-n^{+}$interfaces, we know from Chapter 6 that the potential step height at each of these interfaces is simply $k T / q$ times the natural logarithm of the ratio of the two doping levels. Thus if the doping changes by three orders of magnitude, a typical situation, then the step height is about $7 \mathrm{kT} / \mathrm{q}$, or 0.17 V at room temperature. It turns out that this is a very ineffective barrier to current flow and that these resistances, $R_{3}$ and $R_{7}$, are negligible. The potential step at the contact to the $p^{+}$region is similarly small, and $R_{1}$ is also negligible. The contact to the $n^{+}$region is more troublesome because the potential step height is relatively large and because making a low-resistance contact to $n$-type silicon requires some effort. If aluminum is put on lightly $n$-doped silicon it does not form a low-resistance contact but rather looks like a diode itself; this is called a metal-semiconductor, or Schottky diode (see App. E). To make a low-resistance contact we need to use a heavily doped $n$-region (i.e., an $n^{+}$-region) under the metal, as we have here. Then the depletion region in the $n^{+}$-silicon is so narrow and the electric field at the interface so high that the carriers can readily penetrate right through the barrier. This "tunneling" through a very narrow barrier is a quantum mechanical effect. We will not attempt to model it further in this text. Suffice it to say, however, that it allows us to make low-resistance ohmic contacts to $n$-type silicon in spite of the large electrostatic potential step at the interface and, in this case, to make $R_{9}$ negligible. Thus in a well-designed $p-n$ diode, the only significant impediment to current flow is the $p-n$ junction itself ( $R_{S}$ in Fig. 7.16).

Summarizing, we conclude that in a well-designed $p-n$ junction diode, all of the voltage applied to the external terminals, $v_{\mathrm{AB}}$, appears across the depletion region as a change in the potential step from $\phi_{b}$ to $\phi_{b}-v_{\mathrm{AB}}$. There are two main consequences of this that we will treat in turn next. First, the width of the depletion region changes and, along with it, the net charge, electric field, and electrostatic potential profiles. Second, current flows.

### 7.2 DEPLETION REGION CHANGES

We can still use the depletion approximation model for the $p-n$ junction depletion region unless there is a significant increase in the charge in the depletion region because a current is flowing. When a negative voltage is applied to the $p-n$ diode we will see (as you may already know) that only a very small current flows. It is not difficult to accept that there is little additional charge associated with such a small current. When $v_{\mathrm{AB}}$ is positive, however, much larger currents flow, as we shall see, but even then the charge density of the carriers flowing through the depletion region is much less than the charge density of the ionized donors and acceptors. Thus to an excellent approximation, the net charge distribution $\rho(x)$ can still be assumed to be given by Eq. (6.27), as pictured in Fig. 6.5a. The only difference is that now $x_{n}$ and $x_{p}$ are changed because the potential step is $\phi_{b}-v_{\mathrm{AB}}$ rather than $\phi_{b}$. We will look first at this change and then at its practical implications.

### 7.2.1 Depletion Width Variation with Voltage

The derivation of the electric field and potential profiles through an abrupt $p-n$ junction with an applied bias is identical to what was done in Chap. 6, except that $\phi_{b}$ is replaced everywhere with $\phi_{b}-v_{\mathrm{AB}}$. Thus we can immediately write an expression for the total depletion region width, as well as $x_{n}$ and $x_{p}$, by referring to Eqs. (6.31) and (6.32). The results are

$$
\begin{equation*}
w\left(v_{\mathrm{AB}}\right)=\sqrt{\frac{2 \varepsilon\left(\phi_{b}-v_{\mathrm{AB}}\right)}{q} \frac{N_{A P}+N_{D n}}{N_{A p} N_{D n}}} \tag{7.1}
\end{equation*}
$$

and, as before,

$$
\begin{align*}
& x_{n}=w \frac{N_{A p}}{\left(N_{A p}+N_{D n}\right)}  \tag{7.2a}\\
& x_{p}=w \frac{N_{D n}}{\left(N_{A p}+N_{D n}\right)} \tag{7.2b}
\end{align*}
$$

We see that the depletion region increases with increasingly negative applied voltage and that the increase is roughly as the square root of the magnitude of the voltage. Incidentally, we often call the applied voltage a bias and speak of a negative bias as a reverse bias.

The peak electric field is also changed by the applied bias, similarly increasing with increasing reverse bias. With bias, Eq. (6.34) becomes

$$
\begin{equation*}
\mathscr{E}_{\mathrm{pk}}\left(v_{\mathrm{AB}}\right)=\sqrt{\frac{2 q\left(\phi_{b}-v_{\mathrm{AB}}\right)}{\varepsilon} \frac{N_{A p} N_{D n}}{\left(N_{A p}+N_{D n}\right)}} \tag{7.3}
\end{equation*}
$$

The appearance in Eqs. (7.1) and (7.3) of the term $\left(\phi_{b}-v_{\mathrm{AB}}\right)^{1 / 2}$ raises the concern that there might be a problem if $v_{A B}$ is greater than $\phi_{b}$, at which point the term becomes imaginary. As we shall see, however, we will never encounter this situation because as $v_{A B}$ is increased toward $\phi_{b}$, the current increases exponentially. Long before $v_{A B}$ equals $\phi_{b}$, our assumptions of modest currents, negligible voltage drop elsewhere in the device, negligible charge density in the depletion region due to the charge carrier fluxes, and low-level injection are violated and our model will have to be modified. We will discuss this further in Sec. 7.3.3.

### 7.2.2 Depletion Capacitance

If the voltage bias on a $p-n$ diode is changed, the depletion region width changes, as we have just seen, and some of the current that flows will be that which supplies or removes the charge associated with the change in the depletion region width. If $v_{A B}$ is made more positive, the depletion region decreases and positive charge (i.e., holes) must flow into the $p$-terminal to neutralize some of the depleted acceptors and reduce $x_{p}$, whereas on the $n$-side of the junction, electrons must be supplied to reduce $x_{n}$. Similarly, if $v_{\mathrm{AB}}$ is made more negative, the depletion region widens, some holes must be removed from the $p$-side as $x_{p}$ increases,
and electrons must be removed from the $n$-side as $x_{n}$ increases. This process is pictured in Fig. 7.2.

The depletion region of a $p-n$ diode thus stores charge, a fact that must be included in our modeling of the current-voltage characteristics of a diode. We begin by considering how the charge on the $p$-side of the junction, $q_{\mathrm{DP}}\left(v_{\mathrm{AB}}\right)$, depends on the voltage $v_{\mathrm{AB}}$. The depletion region charge $q_{\mathrm{DP}}\left(v_{\mathrm{AB}}\right)$ on the $p$-side of the junction is given by

$$
\begin{equation*}
q_{\mathrm{DP}}\left(v_{\mathrm{AB}}\right)=-A q N_{A p} x_{p} \tag{7.4}
\end{equation*}
$$

where $A$ is the cross-sectional area of the junction. Using Eq. (6.31b) we have

$$
\begin{equation*}
q_{\mathrm{DP}}\left(v_{\mathrm{AB}}\right)=-A \sqrt{2 \varepsilon q\left(\phi_{b}-v_{\mathrm{AB}}\right) \frac{N_{A p} N_{D n}}{\left(N_{A p}+N_{D n}\right)}} \tag{7.5}
\end{equation*}
$$

We see that the stored charge is a nonlinear function of the applied voltage, so we clearly cannot identify a conventional linear capacitor with the depletion region. However, if the change in voltage is small enough, the corresponding change in the stored charge will be linearly proportional to the change in the voltage. In this case we can define a linear depletion capacitance $C_{\text {dp }}$.


FIGURE 7.2
Changes in the charge distribution in the vicinity of an abrupt $p-n$ junction: (a) as $v_{\mathrm{AB}}$ is increased; $(b)$ as $v_{\mathrm{AB}}$ is decreased.

Imagine that the voltage on the diode, $v_{\mathrm{AB}}$, changes from $V_{\mathrm{AB}}$ to $V_{\mathrm{AB}}+v_{\mathrm{ab}}$, where $\nu_{\mathrm{ab}}$ is "small." The charge $q_{\mathrm{DP}}$ will change from $q_{\mathrm{DP}}\left(V_{\mathrm{AB}}\right)$, which we denote as $Q_{\mathrm{DP}}$, to $q_{\mathrm{DP}}\left(V_{\mathrm{AB}}+v_{\mathrm{ab}}\right.$ ), which we denote as $Q_{\mathrm{DP}}+q_{\mathrm{dp}}$. We know (and will show below) that if $\nu_{\mathrm{ab}}$ is small enough, then $q_{\mathrm{dp}}$ will be linearly related to $v_{\mathrm{ab}}$ as

$$
\begin{equation*}
q_{\mathrm{dp}}=C_{\mathrm{dp}} v_{\mathrm{ab}} \tag{7.6}
\end{equation*}
$$

where $C_{\mathrm{dp}}$ will in general depend on $V_{\mathrm{AB}}$.
There are several ways we might proceed to obtain an expression for $C_{d p}$. One is to consider approximating $q_{D}$ about $V_{\mathrm{AB}}$ using a Taylor series expansion:

$$
\begin{equation*}
q_{\mathrm{DP}}\left(V_{\mathrm{AB}}+\nu_{\mathrm{ab}}\right)=q_{\mathrm{DP}}\left(V_{\mathrm{AB}}\right)+\left.\frac{d q_{\mathrm{DP}}}{d v_{\mathrm{AB}}}\right|_{V_{\mathrm{AB}}} v_{\mathrm{ab}}+\text { Higher-order terms } \tag{7.7}
\end{equation*}
$$

If $v_{\mathrm{ab}}$ is small enough we can neglect the higher-order terms. Doing this and then comparing Eq. (7.7) to Eq. (7.6), we find that

$$
\begin{equation*}
C_{\mathrm{dp}}^{:}\left(V_{\mathrm{AB}}\right)=\left.\frac{d q_{\mathrm{DP}}}{d v_{\mathrm{AB}}}\right|_{V_{\mathrm{AB}}} \tag{7.8a}
\end{equation*}
$$

Another way to get this same result is to take the limit:

$$
\begin{equation*}
C_{\mathrm{dp}}\left(V_{\mathrm{AB}}\right)=\lim _{v_{\mathrm{ab}} \rightarrow 0} \frac{q_{\mathrm{DP}}\left(V_{\mathrm{AB}}+v_{\mathrm{ab}}\right)-q_{\mathrm{DP}}\left(V_{\mathrm{AB}}\right)}{v_{\mathrm{ab}}}=\left.\frac{d q_{\mathrm{DP}}}{d v_{\mathrm{AB}}}\right|_{V_{\mathrm{AB}}} \tag{7.8b}
\end{equation*}
$$

We will use Eq. (7.8a) to define what we mean by the small signal depletion capacitance $C_{\mathrm{dp}}\left(V_{\mathrm{AB}}\right)$ of a junction. Using this definition to evaluate $C_{\mathrm{dp}}\left(V_{\mathrm{AB}}\right)$ for an abrupt $p-n$ junction, we obtain

$$
\begin{equation*}
C_{\mathrm{dp}}\left(V_{\mathrm{AB}}\right)=A \sqrt{\frac{\varepsilon q}{2\left(\phi_{b}-V_{\mathrm{AB}}\right)} \frac{N_{A p} N_{D n}}{\left(N_{A p}+N_{D n}\right)}} \tag{7.9}
\end{equation*}
$$

Summarizing, $C_{\mathrm{dp}}\left(V_{\mathrm{AB}}\right)$ relates the change $q_{\mathrm{dp}}$ in the depletion layer charge $q_{\mathrm{DP}}$ due to a small change $v_{\mathrm{ab}}$ in the applied voltage $v_{\mathrm{AB}}$ about the bias voltage $V_{\mathrm{AB}}$, to the small voltage change $v_{\mathrm{ab}}$ :

$$
\begin{equation*}
C_{\mathrm{dp}}=\frac{q_{\mathrm{dp}}}{v_{\mathrm{ab}}} \tag{7.10}
\end{equation*}
$$

where it is understood that $C_{\mathrm{dp}}$ is a function of $V_{\mathrm{AB}}$.

## Example

Question. Consider two silicon $p$ - $n$ diodes: the first with $N_{A p}$ equal to $4 \times 10^{16} \mathrm{~cm}^{-3}$ and $N_{D n}$ equal to $2.5 \times 10^{15} \mathrm{~cm}^{-3}$; the second with an $N_{A p}$ of $4 \times 10^{16} \mathrm{~cm}^{-3}$ and $N_{D n}$ of $2 \times 10^{17} \mathrm{~cm}^{-3}$. What is the depletion capacitance per unit area of each of these diodes at room temperature for small-signal operation about the following bias points: a) $V_{\mathrm{AB}}=0 \mathrm{~V}$; b) $V_{\mathrm{AB}}=-5 \mathrm{~V}$; and c) $V_{\mathrm{AB}}=+0.4 \mathrm{~V}$ ?

Discussion. Notice that these diodes are the same as those considered in the examples of Chap. 6. We calculated $\phi_{b}$ for these junctions there; substituting those results and the other parameter values into Eq. (7.9), we find that $C_{\text {dp }}$ at zero bias is approximately $1.7 \times 10^{-8} \mathrm{~F} / \mathrm{cm}^{2}$ in the first diode and approximately $6 \times 10^{-8} \mathrm{~F} / \mathrm{cm}^{2}$ in the second.

Because device areas are often measured in microns, a useful unit for area is microns squared, $\mu \mathrm{m}^{2}$. In these terms, $C_{\mathrm{dp}}$ for these two devices is $0.17 \mathrm{fF} / \mu \mathrm{m}^{2}$ and $0.6 \mathrm{fF} / \mu \mathrm{m}^{2}$ for diodes one and two, respectively. The " f " here stands for "femto," the suffix implying a multiplier of $10^{-15}$; that is, 1 fF is equal to $10^{-15} \mathrm{~F}$.

The fact that $C_{\mathrm{dp}}$ is higher in the more heavily doped diode is a general result that reflects the fact that the depletion region is narrower in more heavily doped junctions.

At a reverse bias of -5 V , the depletion capacitances of the two junctions decrease to approximately 0.06 and $0.2 \mathrm{fF} / \mu \mathrm{m}^{2}$, respectively. At a forward bias of 0.4 V , they increase to approximately 0.27 and $0.86 \mathrm{fF} / \mu \mathrm{m}^{2}$, respectively.

If the voltage $v_{a b}$ is a function of time, there will be a current equal to $d q_{\mathrm{dp}} / d t$, into the diode due to this small-signal depletion capacitance. That is,

$$
\begin{equation*}
i=\frac{d q_{\mathrm{dp}}}{d t}=C_{\mathrm{dp}} \frac{d v_{\mathrm{ab}}}{d t} \tag{7.11}
\end{equation*}
$$

We will use this result when we develop circuit models for $p-n$ diodes.
Before leaving our discussion of depletion capacitances, notice that $C_{\mathrm{dp}}$ can be expressed in terms of the depletion region width $w$ when $v_{\mathrm{AB}}=V_{\mathrm{AB}}$. Using Eq. (7.1) in Eq. (7.9), we find that we can write

$$
\begin{equation*}
C_{\mathrm{dp}}\left(V_{\mathrm{AB}}\right)=\frac{\varepsilon A}{w} \tag{7.12}
\end{equation*}
$$

where $w$ is the depletion region width at $v_{\mathrm{AB}}=V_{\mathrm{AB}}$. This is simply the expression for the capacitance of a parallel-plate capacitance of width $w$. It may help to refer to Fig. 7.2 to see that this makes perfect sense. Clearly, any additional charge is added or removed from the outer edges of the depletion region.

### 7.2.3 Applications of the Depletion Capacitance

The linear small signal depletion capacitance associated with a $p-n$ junction turns out to be an extremely useful "device" in its own right. It can, for example, be used in circuits as a voltage-variable capacitor; it can also be used as an analytical tool to characterize the doping profile in a diode. We will discuss each of these applications briefly below.
a) Voltage-variable capacitors. The depletion capacitance clearly depends on the bias voltage $V_{\mathrm{AB}}$, as Eq. (7.9) shows. This fact can be useful in certain circuits as a way of obtaining frequency tunability. You know from other course work that the time constants and resonant frequencies of RC and LRC circuits depend on the sizes of the capacitors in them. If one of those capacitors is a junction depletion
capacitance, its value can be changed by changing the reverse-bias voltage on it. Thus one can adjust, or "tune," the time constants and resonances of the circuit by changing the bias voltage on the relevant junction. A junction designed specifically for such an application is called a varactor.

A word of caution is in order here. You must remember that the charge stored in the depletion region is a nonlinear function of the voltage applied to the junction and that we cannot represent this large signal charge with a linear capacitance. We define a linear depletion capacitance only for small-signal variations about a bias level. The large signal dynamic behavior of RC and LRC circuits containing p-n junctions will in general be complicated to analyze and quite different from what you are familiar with from linear circuit theory. Analyzing the linear behavior for small-signal operation about a bias point, on the other hand, is something very familiar to you.

The bias voltage dependence of $C_{\mathrm{dp}}$ in an abrupt $p-n$ junction is rather weak, and, as you might expect, circuit designers would like capacitors that vary more strongly with bias. The solution is to use diodes with doping profiles that are not abrupt but instead are graded, and furthermore are graded in such a manner that the doping level decreases as one moves away from the junction. This grading is the opposite of that found in a linearly graded or exponentially graded diode (see Sec. 6.3.2) and is much more difficult to obtain. It is, however, commonly used in commercial varactors.
b) Doping profile characterization. A measurement of the small-signal depletion capacitance of a $p-n$ junction as a function of the bias voltage provides a great deal of information on the doping profile in that junction. To appreciate this, rewrite Eq. (7.9) by inverting and squaring it; the result is

$$
\frac{1}{C_{\mathrm{dp}}^{2}}=\frac{2}{\varepsilon q A^{2}} \frac{\left(N_{A p}+N_{D n}\right)}{N_{A p} N_{D n}}\left(\phi_{b}-V_{\mathrm{AB}}\right)
$$

Graphing $1 / C_{\mathrm{dp}}^{2}$ versus $V_{\mathrm{AB}}$ should thus yield a linear plot. If it does not, the junction doping profile is not abrupt and the assumption that Eq. (7.9) is valid is incorrect. (We will discuss this situation in the next paragraph.) If the plot is linear, the junction doping is abrupt and Eq. (7.9) is valid. If we fit a straight line to this plot, the intercept of this line on the voltage axis (i.e., $1 / C_{d p}^{2}=0$ ) is the built-in voltage $\phi_{b}$. The slope of this line contains information on the doping levels on either side of the junction, $N_{A p}$ and $N_{D n}$. If the junction is asymmetrically doped, as is often the case, then the doping-dependent term in the slope, $N_{A p} N_{D n} /\left(N_{A p}+N_{D n}\right)$, is approximately equal to the doping level on the more lightly doped side of the junction. For example, in a $p^{+}-n$ junction, this term is approximately equal to $N_{D n}$, and we have

$$
\begin{equation*}
\frac{1}{C_{\mathrm{dp}}^{2}} \approx \frac{2}{\varepsilon q A^{2} N_{D n}}\left(\phi_{b}-V_{\mathrm{AB}}\right) \tag{7.9b}
\end{equation*}
$$

Thus in an asymmetrically doped junction, the slope of the graph of $1 / C_{d p}^{2}$ versus $V_{\mathrm{AB}}$ tells us the doping level on the more lightly doped side of the junction.

The doping level on the more heavily doped side can then be calculated from $\phi_{b}$ (which, as we have said, we get from the intercept with the horizontal axis, that is, the extrapolation to $1 / C_{\mathrm{dp}}^{2}=0$ ) using Eq. (6.32):

$$
\begin{equation*}
\phi_{b}=\frac{k T}{q} \ln \left(\frac{N_{D n} N_{A p}}{n_{i}^{2}}\right) \tag{6.32}
\end{equation*}
$$

Solving this equation for $N_{A p}$, we have

$$
\begin{equation*}
N_{A p}=\frac{n_{i}^{2}}{N_{D n}} e^{q \phi_{b} / k T} \tag{7.13}
\end{equation*}
$$

At this point you can check that the junction is indeed asymmetrical, as was assumed to obtain $N_{D n}$.

If the graph of $1 / C_{d p}^{2}$ versus $V_{A B}$ is not a straight line, the doping profile is not abrupt but the data on the dependence of $C_{\mathrm{dp}}$ on $V_{\mathrm{AB}}$ may still be very useful. We can show, in fact, that in an asymmetrically doped junction it can give us detailed information on the doping profile on the more lightly doped side of the junction. Specifically, the slope of the $C_{\mathrm{dp}}$ versus $V_{\mathrm{AB}}$ curve at each bias point is proportional to the doping level at the edge of the depletion region on the more lightly doped side of this junction for that same bias level. By changing the bias level and moving the edge of the depletion region through the device, the doping level can be measured as a function of position through the device.

Measurements of this sort are commonly referred to as $C-V$ profiles. They are a very important, widely used characterization technique.

### 7.3 CURRENT FLOW

We have just studied how the depletion region width of a $p-n$ junction changes when we apply bias. The other thing that happens when we bias a $p-n$ junction is that current flows. Our objective in this section is first to understand how this current comes about and then to develop a quantitative model relating the current $i_{\mathrm{D}}$ through a $p-n$ junction diode to the applied voltage $v_{\mathrm{AB}}$.

We argued in Chap. 6 that there can be no net current in thermal equilibrium, and we used this observation to show that in a $p-n$ junction at equilibrium the tendency of the charge carriers to diffuse from the region in which they are in the majority to that in which they are in the minority is counterbalanced by an electric field that develops in the intervening depletion region. Drift (due to the field) and diffusion (due to the concentration gradient) exactly balance, and the current is zero.

When we apply a bias to a $p-n$ junction we change the height of the electrostatic potential barrier at the junction and the magnitude of the electric field in the depletion region, and we disturb the balance between drift and diffusion. For example, consider applying a forward bias, $v_{\mathrm{AB}}>0$. This reduces the electric field and drift, and more carriers can diffuse across the junction. Alternatively, we can say that the barrier height is reduced and that more carriers can surmount it. In either case, a current flows and the magnitude of this current increases as we ap-
ply more forward bias, further lowering the barrier to diffusion and, equivalently, further reducing the drift field.

When we apply a reverse bias, the potential barrier height is increased along with the magnitude of the electric field and there will be a net current in the reverse (by convention "negative") direction. However, it will not be a very large current because there are very few electrons on the $p$-side of the junction and there are very few holes on the $n$-side of the junction to drift across. The few minority carriers that wander to the edge of depletion region and experience the large field are quickly swept across the junction, to be sure, but there are so few of these carriers that the current remains small even at very high reverse-bias levels.

To quantify the above discussion we will pursue a line of reasoning first presented by William Shockley in the late 1940s. Shockley pointed out that except at very high current levels-and we will be able to quantify what we mean by "very high" later-our $p-n$ diode can be divided into three regions: the depletion region and two quasineutral regions (one on the $p$-side and one on the $n$-side of the junction). This is illustrated in Fig. 7.3. The quasineutral regions can be treated using the techniques we developed for solving flow problems in Chap. 5 as long as low-level injection conditions are satisfied. We simply need to know the boundary conditions on the excess minority carrier populations on either side of the depletion region, that is, $p^{\prime}\left(x_{n}\right)$ and $n^{\prime}\left(-x_{p}\right)$, and we can get these by extending the models introduced in Chap. 6. Given the boundary conditions, we can solve the flow problems in the two quasineutral regions to find the minority carrier currents there. Knowing the minority carrier currents on either side of the depletion region, we relate them across this region and in a straightforward manner obtain an expression for the total diode current.

We thus first turn our attention to a consideration of modeling the excess populations, $n^{\prime}$ and $p^{\prime}$, on either side of the depletion region, then to solving the relevant flow problems in the quasineutral regions, and finally to getting the current-voltage relationship. Once we obtain our result we will look back at what


FIGURE 7.3
Identification of the depletion region and the two quasineutral regions in a general $p-n$ junction diode.
assumptions and approximations we have made and will discuss the limitations of our model.

### 7.3.1 Excess Populations at the Depletion Region Edges

To understand how we can model the minority carrier populations at the edges of the depletion region, we begin by again considering the structure in thermal equilibrium. Looking first at the holes, we have $p_{0}\left(-x_{p}\right)=N_{A p}$ and $p_{o}\left(x_{n}\right)=$ $n_{i}^{2} / N_{D n}$. Dividing these two expressions relates the hole population on one side of the depletion region to that on the other:

$$
p_{o}\left(x_{n}\right)=\frac{p_{o}\left(-x_{p}\right) n_{i}^{2}}{N_{D n} N_{A p}}
$$

Referring back to Eq. (6.32),

$$
\begin{equation*}
\phi_{b}=\frac{k T}{q} \ln \left(\frac{N_{D n} N_{A p}}{n_{1}^{2}}\right) \tag{6.32}
\end{equation*}
$$

we can relate the factor $n_{i}^{2} /\left(N_{D_{n}} N_{A p}\right)$ to the potential barrier at the junction, that is,

$$
\frac{n_{i}^{2}}{N_{D n} N_{A p}}=e^{-q \phi_{b} / k T}
$$

and we see that $p_{o}\left(x_{n}\right)$ can be written as

$$
\begin{equation*}
p_{o}\left(x_{n}\right)=p_{o}\left(-x_{p}\right) e^{-q \phi_{b} / k T} \tag{7.14}
\end{equation*}
$$

Equation (7.14) reflects a useful result from statistical thermodynamics that models the energy distribution of particles such as holes and electrons. Specifically it tells us that the particles in any population at thermal equilibrium have a distribution of thermal energies. Many have low thermal energy, and fewer have higher amounts of energy. Mathematically we say that if the concentration with energy $E_{1}$ or greater is $c_{1}$, then the concentration $c_{2}$ with energy $E_{2}$ or greater, where $E_{2}>E_{1}$, is $c_{1} e^{-\left(E_{2}-E_{1}\right) / k T}$. In other words,

$$
\begin{equation*}
c_{2}\left(E \geq E_{2}\right)=c_{1}\left(E \geq E_{1}\right) e^{-\left(E_{2}-E_{1}\right) / k T} \tag{7.15}
\end{equation*}
$$

Returning now to Eq. (7.14) and the holes, the variation in the electrostatic potential energy of holes $q \phi$ encountered in moving from one side of a junction to the other is illustrated in Fig. 7.4. At $x=-x_{p} ; \phi$ is $\phi_{p}$ and the population of holes with energy greater than $q \phi_{p}$ is $p_{o}\left(-x_{p}\right)$. As we move to the right of $-x_{p}$, the potential energy increases and thus the population of holes should decrease because fewer and fewer have that much energy. We have a potential energy "hill" for holes that rises a total of $q \phi_{b}$ up to a height of $q \phi_{n}$ at $x=x_{n}$. The population of holes with sufficient energy to surmount the hill (i.e., with more


FIGURE 7.4
Potential energy hill for holes at an abrupt $p-n$ junction in thermal equilibrium.
energy than $q \phi_{n}$ ) should be related to the total population at the bottom of the hill according to Eq. (7.15) as follows:

$$
\begin{equation*}
p_{o}\left(x_{n}\right)=p_{o}\left(-x_{p}\right) e^{-q \phi_{b} / k T} \tag{7.14}
\end{equation*}
$$

This is just Eq. (7.14) again. Stating this in words, we say that the hole population is in thermal equilibrium with the potential barrier at the junction. The population to the right of the barrier is related to the population to the left of the barrier by the Boltzman factor, $e^{-q \phi_{b} / k T}$.

The electron population is also in thermal equilibrium with the potential barrier, but because the potential energy of electrons is $-q \phi$, the low side of the hill is to the right for $n$-type material and the "top" is to the left. You can easily show that the equivalent to Eq. (7.14) for electrons is

$$
\begin{equation*}
n_{o}\left(-x_{p}\right)=n_{o}\left(x_{n}\right) e^{-q \phi_{b} / k T} \tag{7.16}
\end{equation*}
$$

Thus far we have been in thermal equilibrium, but now we want to apply a voltage $v_{A B}$. The potential barrier at the junction changes from $\phi_{b}$ to $\phi_{b}-v_{A B}$, but what happens to the carrier populations? We look first at the majority carrier populations, specifically the hole population on the $p$-side. Assume that we maintain low-level injection conditions in the $p$-side to the left of $-x_{p}$, so that the hole population at $-x_{p}$ remains unchanged at $N_{\text {Ap }}$. Further assume that the hole population can maintain itself in equilibrium with the potential barrier throughout the depletion region, that is, up to $x=x_{n}$. Past that point (i.e., for $x>x_{n}$ ), the holes are minority carriers in a quasineutral region and their motion is limited by their diffusion away from the edge of the depletion region into the $n$-side. Saying that the holes maintain themselves in equilibrium with the potential barrier in the depletion region means that the holes can move across this region
rather freely. The depletion region does not represent a bottleneck, as it were, to their motion, whereas diffusion in the quasineutral region, which is in series with it, does.

If we can say that the holes are in equilibrium with the barrier, it must still be true that $p\left(-x_{p}\right)$ and $p\left(x_{n}\right)$ are related by a Boltzmann factor, which in this case is $e^{-q\left(\phi_{b}-\nu_{A B}\right) / k T}$. That is,

$$
\begin{equation*}
p\left(x_{n}\right)=p\left(-x_{p}\right) e^{-q\left(\phi_{b}-v_{\mathrm{AB}}\right) / k T} \tag{7.17a}
\end{equation*}
$$

Furthermore, as long as low-level injection conditions are maintained, we will have $p\left(-x_{p}\right) \approx p_{o}\left(-x_{p}\right)$. Thus

$$
\begin{equation*}
p\left(x_{n}\right) \approx p_{o}\left(-x_{p}\right) e^{-q\left(\phi_{b}-v_{\mathrm{AB}}\right) / k T} \tag{7.17b}
\end{equation*}
$$

This situation is illustrated in Fig. 7.5.
Eq. (7.17b) can be written in terms of the equilibrium hole population at $x_{n}$ using Eq. (7.14). We have

$$
\begin{equation*}
p\left(x_{n}\right)=p_{o}\left(x_{n}\right) e^{q v_{\mathrm{AB}} / k T} \tag{7.17c}
\end{equation*}
$$

and because we know that $p_{0}\left(x_{n}\right)=n_{i}^{2} / N_{D n}$ we have

$$
\begin{equation*}
p\left(x_{n}\right)=\frac{n_{i}^{2}}{N_{D n}} e^{q v_{\mathrm{AB}} / k T} \tag{7.17d}
\end{equation*}
$$

Finally, the excess hole population at $x_{n}, p^{\prime}\left(x_{n}\right)$ [which is $p\left(x_{n}\right)-p_{o}\left(x_{n}\right)$ ] is given by

$$
\begin{equation*}
p^{\prime}\left(x_{n}\right)=\frac{n_{i}^{2}}{N_{D n}}\left(e^{q \nu_{A B} / k T}-1\right) \tag{7.18}
\end{equation*}
$$

Potential energy of holes


FIGURE 7.5
Potential energy barrier for holes and the hole populations on either side of a biased $p-n$ junction.

Similarly we can argue that the electron population stays in equilibrium with the barrier, and we find that

$$
\begin{equation*}
n^{\prime}\left(-x_{p}\right)=\frac{n_{i}^{2}}{N_{A p}}\left(e^{q v_{\mathrm{AB}} / k T}-1\right) \tag{7.19}
\end{equation*}
$$

These excess minority carrier populations are the boundary conditions we need to solve for the minority carrier currents in the $p$ - and $n$-regions of the diode and to ultimately calculate the total diode current.

### 7.3.2 Current-Voltage Relationship for an Ideal Diode

Having established the boundary conditions at either side of the depletion region of a biased $p-n$ junction, we are in a position to solve the flow problems in the two quasineutral regions. Looking first at the $n$-side of the junction, we have $p^{\prime}\left(x_{n}\right)$ given by Eq. (7.18), $p^{\prime}\left(w_{n}\right)=0$, and $g_{L}(x)=0$. The solution for $p^{\prime}(x)$ for $x_{n} \leq x \leq w_{n}$ is

$$
\begin{equation*}
p^{\prime}(x)=p^{\prime}\left(x_{n}\right) \frac{\sinh \left[\left(w_{n}-x\right) / L_{h}\right]}{\sinh \left[\left(w_{n}-x_{n}\right) / L_{h}\right]} \tag{7.20}
\end{equation*}
$$

This result is illustrated in Fig. 7.6a.
The hole current on the $n$-side for $x_{n} \leq x \leq w_{n}$ is therefore

$$
\begin{equation*}
J_{h}(x)=q \frac{D_{h} p^{\prime}\left(x_{n}\right)}{L_{h}} \frac{\cosh \left[\left(w_{n}-x\right) / L_{h}\right]}{\sinh \left[\left(w_{n}-x_{n}\right) / L_{h}\right]} \tag{7.21}
\end{equation*}
$$

Substituting Eq. (7.18) for $p^{\prime}\left(x_{n}\right)$ into this result, we obtain

$$
\begin{equation*}
J_{h}(x)=q \frac{D_{h}}{L_{h}} \frac{\cosh \left[\left(w_{n}-x\right) / L_{h}\right]}{\sinh \left[\left(w_{n}-x_{n}\right) / L_{h}\right]} \frac{n_{i}^{2}}{N_{D n}}\left(e^{q v_{A B} / k T}-1\right) \tag{7.22}
\end{equation*}
$$

Following the same reasoning to find the excess minority carrier (electron) population on the $p$-side and then calculating the diffusion current, we find $J_{e}(x)$ for $-w_{p} \leq x \leq-x_{p}$ to be

$$
\begin{equation*}
J_{e}(x)=q \frac{D_{e}}{L_{e}} \frac{\cosh \left[\left(w_{p}-x\right) / L_{e}\right]}{\sinh \left[\left(w_{p}-x_{p}\right) / L_{e}\right]} \frac{n_{i}^{2}}{N_{A p}}\left(e^{q v_{A \mathrm{AB}} / k T}-1\right) \tag{7.23}
\end{equation*}
$$

These results are illustrated in Fig. 7.6b.
We almost have our answer. We want the total current, which we know is the sum of the electron and hole currents and is not a function of $x$. Thus if we knew both the hole and the electron currents at one point $x$, we could add them together and know the total current. The problem is that we don't know the hole and electron currents at the same $x$. We know $J_{h}(x)$ for $x_{n}<x<w_{n}$, and we know $J_{e}(x)$ for $-w_{p}<x<-x_{p}$, but these two spans do not overlap.

We proceed by assuming that there is negligible generation or recombination in the depletion region. That is, we say that the only holes that flow out of the depletion region at $x=x_{n}$ are the ones that entered at $x=-x_{p}$.


FIGURE 7.6
(a) Excess carrier populations in a forward-biased $p-n$ junction diode; (b) the corresponding minority carrier diffusion current densities on either side of the junction; (c) the connection of the currents through the depletion region to obtain total current density.

Thus

$$
\begin{equation*}
J_{h}\left(x_{n}\right)=J_{h}\left(-x_{p}\right) \tag{7.24}
\end{equation*}
$$

It follows that the same thing must then be true for the electrons:

$$
\begin{equation*}
J_{e}\left(-x_{p}\right)=J_{e}\left(x_{n}\right) \tag{7.25}
\end{equation*}
$$

These results are illustrated in Fig. 7.6c. With this assumption we can immediately write

$$
\begin{equation*}
J_{\mathrm{TOT}}=J_{e}\left(-x_{p}\right)+J_{h}\left(x_{n}\right) \tag{7.26}
\end{equation*}
$$

Using Eqs. (7.22) and (7.23) in Eq. (7.26), we find

$$
\begin{equation*}
J_{\mathrm{TOT}}=q n_{i}^{2}\left(\frac{D_{e}}{N_{A p} w_{p}^{*}}+\frac{D_{h}}{N_{D n} w_{n}^{*}}\right)\left(e^{q \nu_{A B} / k T}-1\right) \tag{7.27}
\end{equation*}
$$

where $w_{p}^{*}$ and $w_{n}^{*}$ are the effective widths of the $p$ - and $n$-sides, respectively, defined as

$$
\begin{align*}
& w_{p}^{*} \equiv L_{e} \tanh \left[\left(w_{p}-x_{p}\right) / L_{e}\right]  \tag{7.28a}\\
& w_{n}^{*} \equiv L_{h} \tanh \left[\left(w_{n}-x_{n}\right) / L_{h}\right] \tag{7.28b}
\end{align*}
$$

Often we will be in either of two limits: the short-base limit, which corresponds to the situation when the minority carrier diffusion length is much greater than the width of the device, and the long-base limit, which corresponds to the situation when the minority carrier diffusion length is much smaller than the width of the device. Looking first at the short-base limit, if we assume, for example, that $L_{e} \gg w_{p}$, we find that Eq. (7.28a) reduces to $w_{p}^{*} \approx w_{p}-x_{p}$. In general, in the short-base limit the effective width of the relevant side of the device is the actual physical width of the corresponding quasineutral region.

Turning next to the long-base limit, if we assume that $L_{e} \ll w_{p}$, then Eq. (7.28a) reduces to $w_{p}^{*} \approx L_{e}$. In general, in the long-base limit the effective width of the relevant side of the device is the minority carrier diffusion length.

To illustrate these two limiting cases, and to compare them with the intermediate situation, refer to Fig. 7.7. In this figure, the hole and electron currents are plotted as a function of position throughout a $p-n$ diode for three cases: $L_{e} \approx w_{p}$ and $L_{h} \approx w_{n} ; L_{e} \gg w_{p}$ and $L_{h} \gg w_{n}$ (that is, short base); and $L_{e} \ll w_{p}$ and $L_{h} \ll w_{n}$ (that is, long base).

The total diode current is the total current density multiplied by the crosssectional area of the diode, $A$. Thus

$$
i_{D}=A J_{\mathrm{TOT}}
$$

We often write

$$
\begin{equation*}
i_{D}=I_{S}\left(e^{q v_{\mathrm{AB}} / k T}-1\right) \tag{7.29}
\end{equation*}
$$

and we can now write the saturation current $I_{S}$ as

$$
\begin{equation*}
I_{S}=A q n_{i}^{2}\left(\frac{D_{e}}{N_{A p} w_{p}^{*}}+\frac{D_{h}}{N_{D n} w_{n}^{*}}\right) \tag{7.30}
\end{equation*}
$$



FIGURE 7.7
Current density profiles through a forward-biased abrupt p-n junction diode in three cases: (a) $L_{\min } \approx w$; (b) $L_{\min } \gg w$; (c) $L_{\min } \ll w$.

The current-voltage relationship for an ideal exponential diode, Eq. (7.29), is plotted as the solid curve in Fig. 7.8.

## Example

Question. Consider the two diodes in the preceding example. Assume that the effective widths of the $n$ - and $p$-sides of these devices, $w_{n}^{*}$ and $w_{p}^{*}$, is $1 . \mu \mathrm{m}$, and that $D_{e}$ is $40 \mathrm{~cm}^{2} / \mathrm{s}$ and $D_{h}$ is $15 \mathrm{~cm}^{2} / \mathrm{s}$. What are the relative sizes of the saturation current densities of these two diodes?

Discussion. We must use Eq. (7.30) to answer this question. Substituting the appropriate values into this expression, we calculate that $J_{s}$ is $2.4 \times 10^{-9} \mathrm{~A} / \mathrm{cm}^{2}$ for the first diode and $3.6 \times 10^{-10} \mathrm{~A} / \mathrm{cm}^{2}$ for the second. The ratio is 6.7 to 1 , with the lightly doped diode showing the higher current.

When $v_{\mathrm{AB}}$ is more than a few $k T / q$ positive, the 1 in Eq. (7.29) is negligible and we can write

$$
\begin{equation*}
i_{D} \approx I_{S} e^{q \nu_{\mathrm{AB}} / k T} \quad \text { when } \quad v_{\mathrm{AB}} \gg \frac{k T}{q} \tag{7.31}
\end{equation*}
$$

The diode current increases exponentially, which means that it does so relatively quickly. At room temperature it increases by a factor of 10 every 60 mV (roughly $2.3 \mathrm{kT} / \mathrm{q}$ at 300 K ). The saturation current $I_{S}$ is itself generally very, very small, but because of the exponential multiplier, $i_{D}$ can be large.

When $v_{A B}$ is more than a few $k T / q$ negative, the exponential factor is negligible and the current remains fixed at $-I_{S}$. We refer to this as $i_{D}$ "saturating" at $-I_{S}$ in reverse bias and write

$$
\begin{equation*}
i_{D} \approx-I_{S} \quad \text { when } \quad v_{A B} \ll \frac{-k T}{q} \tag{7.32}
\end{equation*}
$$

This "reverse" current is very small, essentially zero when compared to the current flowing under forward bias. Physically, the current under reverse bias is limited to a small value because there are so few electrons on the $p$-side of the junction and so few holes on the $n$-side. The minority carrier concentrations at the edges of the space charge layer go to zero when the junction is reverse-biased by more than a few $k T / q$, so at $-x_{p}$ the excess electron concentration is $-n_{p o}$ and at $x_{n}$ the excess hole concentration is $-p_{n o}$, as shown in Fig. 7.9. This is as negative as these excesses can get, so the diffusion-driving concentration gradient cannot become any larger either, even if the magnitude of the reverse bias becomes very large. Thus the current saturates and does so at a very low level. Under forward bias, by contrast, there is no limit to how large the excess populations and the concentration gradients can get; accordingly, the forward current can be very much larger than the reverse current.

Returning to our expression $I_{S}$ [e.g., Eq. (7.30)]:

$$
\begin{equation*}
I_{S}=A q n_{i}^{2}\left(\frac{D_{e}}{N_{A p} w_{p}^{*}}+\frac{D_{h}}{N_{D n} w_{n}^{*}}\right) \tag{7.30}
\end{equation*}
$$



FIGURE 7.8
Current-voltage relationship for a p-n junction on a semilog scale:
(a) forward bias; (b) reverse bias. [The solid curve is the ideal exponential diode expression, Eq $(7.29)$, and the dashed curve is typical of what one would measure for a real diode (see Sec. 7.3.3).]


FIGURE 7.9
(a) The excess carrier populations in a reverse-biased $p$ - $n$ junction; (b) the corresponding current densities. (Except for $x_{n}$ and $x_{p}$, these plots do not change with increasing reverse bias once $\nu_{\mathrm{AB}}$ is more than a few $k T / q$ negative.)
we see that the doping levels on both sides of the junction play a major role in determining both the magnitude of the current and whether the junction current is carried primarily by holes or electrons. The device dimensions and carrier transport parameters also enter this expression, but in most diodes the effective widths of the $n$ - and $p$-sides tend to be of the same order of magnitude; so do the minority carrier diffusion coefficients. The doping levels, on the other hand, can be varied over many orders of magnitude by the device designer to modify the magnitude and make-up of $I_{S}$. For example, Eq. (7.30) tells us that $I_{S}$ is larger in more lightly doped junctions. It also tells us that if $N_{A p} \gg N_{D n}$, the current will consist primarily of holes flowing, or "injected," from the $p$-side into the $n$ side. On the other hand, if $N_{D n} \gg N_{A p}$, the current will primarily be electrons injected into the $p$-side. This ability to control the nature of the junction current is very important in the design of bipolar transistors and other devices involving $p-n$ junctions.

## Example

Question. Consider again the two diodes in the preceding example. What is the ratio of electron current to hole current crossing the junction in each of these devices?

Discussion. Looking back at Eqs. (7.22) and (7.23) we see that the ratio of electron to hole current across the junction is given by $D_{e} N_{D n} w_{n}^{*} / D_{h} N_{A p} w_{p}^{*}$. Upon evaluating this factor we find that it is 0.17 , or $1 / 6$, for the first diode and 13 for the
second. We see that electrons dominate the current in the diode that has its $n$-side more heavily doped than its $p$-side (diode \#2), whereas holes dominate when the $p$-type side is the more heavily doped (diode $\# 1$ ). We must be careful generalizing here because the diffusion coefficients and effective widths, as well as the doping levels, enter this relation, but the relative doping level is a very useful parameter to use to control injection across a junction.

### 7.3.3 Limitations to the Simple Model

If we plot the ideal diode current-voltage relationship, Eq. (7.29), on a semilog plot, we obtain the curve given by the solid line in Fig. 7.8. If we then measure a real $p$ - $n$ diode and plot its current-voltage relationship on the same graph, the data will typically look more like the dashed curve in Fig. 7.8. The general shapes of the curves are similar, and they agree quantitatively over a substantial range of forward biases, but there are important differences at low and high current levels. We want now to understand the reason for these differences and to decide whether they present serious problems. We begin by examining the region of low biases and then considering large forward and reverse biases.
a) Low current levels. At low forward-bias levels and low to moderate reversebias levels, where the magnitude of the current is ideally on the order of $I_{S}$ or less, we find in actual diodes that the magnitude of the current is considerably higher than $I_{S}$. More extensive study of the "extra" current reveals that it is due to generation and recombination in the depletion region. In forward bias there are excess holes and electrons in the depletion region, and we should anticipate that there will be some recombination in the depletion region. In our ideal diode model we neglected this recombination and arrived at Eqs. (7.24) and (7.25). In order to include a depletion region recombination current, assume that the total recombination in the depletion region is $R\left(v_{\mathrm{AB}}\right)$ hole-electron pairs $/ \mathrm{cm}^{2} \cdot \mathrm{~s}$, which, as we have indicated, will be a function of the applied voltage. The hole current due to this recombination is $q R$, and the electron current is $-q R$.

To relate the currents in and out of the depletion region we now note that if there is recombination in the depletion region more holes must flow in from the left than flow out to the right (assuming an orientation like that in Fig. 7.1). Defining $J_{R}$ as $q R$, we thus write

$$
\begin{equation*}
J_{h}\left(-x_{p}\right)=J_{h}\left(x_{n}\right)+J_{R} \tag{7.33a}
\end{equation*}
$$

For electrons, more electrons must flow in from the right than flow out to the left. The correct expression is

$$
\begin{equation*}
J_{e}\left(-x_{p}\right)+J_{R}=J_{e}\left(x_{n}\right) \tag{7.33b}
\end{equation*}
$$

Thus, the total current is now

$$
\begin{equation*}
J_{\mathrm{TOT}}=J_{e}\left(-x_{p}\right)+J_{h}\left(x_{n}\right)+J_{R} \tag{7.34}
\end{equation*}
$$

which is the ideal diode current plus $J_{R}$.
$J_{R}$ is itself a function of the applied voltage. It turns out that a good approximate model for $J_{R}$ is that it varies exponentially with $v_{\mathrm{AB}}$ as $e^{q \nu_{\mathrm{AB}} / n k T}$ for
$v_{\mathrm{AB}} \gg k T / q$, where $n$ is approximately 2 . The factor of two in the denominator of the exponential means that $J_{R}$ does not increase as quickly with increasing bias $v_{A B}$ as does the ideal diffusion current and that at sufficiently high forward bias the ideal relationship dominates. This variation is illustrated in Fig. 7.8a.

The factor of two in the denominator of the exponential in $J_{R}$ arises because of the fact that the carriers halfway up the potential hill on either side of the junction barrier are the most active in the recombination process. The model that is used to describe this process is called the Shockley-Read-Hall model, but we will not study it specifically in this text. Our primary concern is to learn that if we go to very low currents our ideal model may be incomplete; beyond that we will simply try to avoid working at such low current levels.

For reverse biases, there is a deficiency rather than an excess of holes and electrons in the depletion region and generation rather than recombination. Additional holes and electrons are created in the depletion region, so more flow out than flow in. If the generation is $G$, then the hole generation current will be $-q G$ and the electron generation current will be $q G$. $G$ will be only a weak function of $v_{A B}$ because the depletion region width will increase slightly with increasingly negative $v_{\mathrm{AB}}$. If we neglect this effect, to first order we can write a general depletion region generation-recombination current as

$$
\begin{equation*}
J_{\mathrm{GR}}=J_{\mathrm{GRS}}\left(e^{q v_{\mathrm{AB}} / 2 k T}-1\right) \tag{7.35}
\end{equation*}
$$

and, writing $A J_{\mathrm{GRS}}$ as $I_{\mathrm{GRS}}$, we can write the total current as

$$
\begin{equation*}
i_{D}=I_{S}\left(e^{q \nu_{\mathrm{AB}} / k T}-1\right)+I_{\mathrm{GRS}}\left(e^{q \nu_{\mathrm{AB}} / 2 k T}-1\right) \tag{7.36}
\end{equation*}
$$

$I_{\mathrm{GRS}}$ is typically much greater than $I_{S}$.
You need not be concerned with learning Eq. (7.36). The important message is that depletion region generation and recombination have a weaker dependence on applied bias $v_{\mathrm{AB}}$ than the diffusion currents, so that at sufficiently high forward bias the ideal behavior will dominate. This is where we will want to operate $p$ $n$ junctions used in bipolar transistor emitter-base junctions. It is also why we use high-purity single crystals to make $p-n$ diodes; if we did not, $J_{\text {GRS }}$ would be so large that the ideal behavior might never dominate the junction current. In building diodes we always want to minimize $J_{\mathrm{GRS}}$.
b) Large forward bias. At large forward biases the current does not increase as quickly as the ideal diode expression indicates that it should. Two effects account for this. The first is that at high current levels we can no longer neglect resistive voltage drops in the bulk $n$ - and $p$-regions of the diode ( $R_{4}$ and $R_{6}$ in Fig. 7.1b). Thus the entire applied voltage $v_{\mathrm{AB}}$ does not appear across the junction but rather is reduced by $i_{D}\left(R_{4}+R_{6}\right)$. Our current-voltage relation at high current levels becomes transcendental:

$$
\begin{equation*}
i_{D}=I_{S} e^{q\left(v_{A B}-i_{D} R\right) / k T} \tag{7.37}
\end{equation*}
$$

where $R \equiv R_{4}+R_{6}+$ any other series resistances.
The second effect that becomes important at high current levels is high-level injection into the quasineutral regions. Our entire diffusive flow model becomes
questionable then, and we have a much more difficult problem to treat analytically. Interestingly, if we include high-level injection in our boundary condition model, Eqs. (7.18) and (7.19), we find that the excesses increase only as $e^{q \nu_{\mathrm{AB}} / 2 k T}$ at high injection levels. A factor of two now appears in the denominator, and again the rate of increase is less than the ideal diode equation would predict.

The onset of high-level injection is often taken to be the point at which the excess minority carrier population on either side of the junction equals some percentage of the equilibrium majority carrier population; in an asymmetric diode this occurs first on the more lightly doped side of the junction. Suppose, for example, that we have an $n^{+}-p$ junction with a doping level on the $p$-side of $N_{A p}$ and that high-level injection occurs when $n_{p}^{\prime} \geq N_{A p}$. Using Eq. (7.19) we thus see that the junction voltage at the onset of high-level injection is given by

$$
\begin{equation*}
V_{\mathrm{AB}}=\frac{2 k T}{q} \ln \frac{N_{A p}}{n_{i}} \tag{7.38}
\end{equation*}
$$

As was the case at low current levels, our main concern in this text is to realize that there is a limit to ideal diode behavior at high current levels. In general, we want to operate below this limit.
c) Large reverse voltages. At large reverse biases the current in any real diode will suddenly increase abruptly. We call this phenomenon reverse breakdown, but it is not necessarily a destructive process. It is, in fact, used in several important devices, namely voltage reference diodes and avalanche photodiodes. The sharp increase in reverse current when a diode junction breaks down is due to a sharp increase in the depletion region generation current caused by one of two mechanisms. In most junctions, the few carriers flowing across the junction in reverse bias gain enough energy because of the large potential energy step that if they happen to collide with an electron in a bond they can knock it free. The carrier pair created and the original carrier can in turn accelerate, collide with more bonds, and create still more hole-electron pairs. An avalanche of carriers is suddenly created. This process is called avalanche breakdown.

In very heavily doped junctions, the depletion region is very narrow and the electric field is very large. The distances are too short for an avalanche to build up. Instead, breakdown occurs when the fields get so intense that electrons can actually be torn from the bonds; hole-electron pairs are generated in this fashion. This process is called Zener breakdown, after the man who first suggested it.

We often model breakdown by saying that it occurs when the electric field in a junction reaches a critical value $\mathscr{E}_{\text {CRIT }}$, which to first order we take to be constant for a given material. Using Eq. (7.3), we see that the breakdown voltage $V_{B R}$ is

$$
\begin{equation*}
V_{\mathrm{BR}} \approx-\frac{\varepsilon^{\varepsilon} \varepsilon_{\mathrm{CRIT}}^{2}}{2 q} \frac{\left(N_{A p}+N_{D n}\right)}{N_{A p} N_{D n}} \tag{7.39}
\end{equation*}
$$

Looking at this expression, we see that the last term is dominated by the doping level of the more lightly doped side of the junction and that $\left|V_{B R}\right|$ varies inversely
with that doping level (i.e., it is larger for a lightly doped junction than for a heavily doped junction).

Because reverse breakdown is so sharp and is not destructive, it is often used to provide a voltage reference. Both breakdown processes occur at very specific peak electric field intensities, and it is possible through suitable selections of $N_{A p}$ and $N_{D n}$ to design diodes to break down at specific applied voltages using Eq. (7.3) and knowledge of the breakdown field of the semiconductor being used.

### 7.3.4 Diffusion Capacitance

In Sec. 7.2 .2 we pointed out that stored charge was associated with the depletion regions that varied with the applied voltage and looked from the device terminals like a nonlinear capacitor. There is also stored charge associated with the excess carrier populations on either side of a biased $p-n$ junction. This charge also varies with the applied bias and also looks like a nonlinear capacitor. We call this the diffusion capacitance. We will define a linear, small-signal diffusion capacitance $C_{\mathrm{df}}$ in a manner similar to the one we used for the depletion capacitance.

To minimize confusion we will treat an asymmetrically doped junction, so that minority carriers are injected primarily into only one side of the junction, and we will treat a short-base diode. The model is easily generalized to arbitrary doping levels and diffusion lengths, but treating the general case is unnecessarily complex. Assume that we have an abrupt $p^{+}-n$ junction, that $L_{h} \gg w_{n}$, and that we have cross-sectional area $A$. The excess carrier profile through such a


FIGURE 7.10
Excess hole and electron profile in a forward-biased asymmetric abrupt $p^{+}-n$ junction.
device under forward bias is shown in Fig. 7.10. For a given applied bias $v_{A B}$, the total excess hole concentration on the $n$-side of the junction, $p_{n}^{\prime}\left(v_{\mathrm{AB}}\right)$, is given by

$$
\begin{equation*}
p_{n}^{\prime}\left(v_{\mathrm{AB}}\right)=A \frac{\left(w_{n}-x_{n}\right) n_{i}^{2}}{2 N_{D n}}\left(e^{q v_{\mathrm{AB}} / k T}-1\right) \tag{7.40}
\end{equation*}
$$

The total concentration of excess electrons is exactly the same because quasineutrality is a valid assumption, at least for low-level injection. The interesting thing about the stored positive and negative charge associated with these excess hole and electron populations is that they occupy the same physical space, $x_{n}<x<w_{n}$. This is in contrast to a standard capacitor, where the positive charge is on one of two capacitor plates and the negative charge is on the other. Nonetheless, the excess populations do represent stored charge, and when the applied voltage is increased (or decreased), additional positive and negative carriers have to be added to it (or removed), as Fig. 7.11 illustrates. The positive charge is supplied from (or removed through) the $p$-side of the junction and the electrons via the $n$-side.

(a) Positive change in $v_{\mathrm{AB}}$


FIGURE 7.11
Changes in excess hole and electron populations: (a) for an increase in applied voltage; (b) for a decrease in applied voltage.

Following the same process that we used with the depletion capacitance in Section 7.2.2, we first get an expression for the total excess positive charge $q_{\mathrm{DF}}$ (i.e., that due to excess holes). Using Eq. (7.40), we have

$$
\begin{equation*}
q_{\mathrm{DF}}\left(v_{\mathrm{AB}}\right)=q A \frac{\left(w_{n}-x_{n}\right)}{2} \frac{n_{i}^{2}}{N_{D n}}\left(e^{q v_{\mathrm{AB}} / k T}-1\right) \tag{7.41}
\end{equation*}
$$

Again we see that the charge is a nonlinear function of the applied voltage. For small changes in applied voltage, however, the change in $q_{\mathrm{DF}}$ will be linearly proportional to the change in the applied voltage. Again we assume that the applied voltage changes from $V_{\mathrm{AB}}$ to $V_{\mathrm{AB}}+\nu_{\mathrm{ab}}$ and find the change in $q_{\mathrm{DF}}$, which we will denote as $q_{\mathrm{df}}$. We will call the ratio of $q_{\mathrm{df}}$ to $v_{\mathrm{ab}}$ the diffusion capacitance $C_{\mathrm{df}}$ of the junction at this bias point. That is,

$$
\begin{equation*}
\frac{q_{\mathrm{df}}}{v_{\mathrm{ab}}}=C_{\mathrm{df}} \tag{7.42}
\end{equation*}
$$

Clearly this ratio must equal the derivative of $q_{\mathrm{DF}}$ with respect to $v_{\mathrm{AB}}$ at $V_{\mathrm{AB}}$ :

$$
\begin{equation*}
\left.C_{\mathrm{df}} \equiv \frac{d q_{\mathrm{DF}}}{d v_{\mathrm{AB}}}\right|_{v_{\mathrm{AB}}=V_{\mathrm{AB}}} \tag{7.43}
\end{equation*}
$$

We will take Eq. (7.43) as a general definition of the diffusion capacitance of a junction.

Using Eq. (7.41), we find for an abrupt $p^{+}-n$ junction that

$$
\begin{equation*}
C_{\mathrm{df}}\left(V_{\mathrm{AB}}\right)=q^{2} A \frac{\left(w_{n}-x_{n}\right)}{2 k T} \frac{n_{i}^{2}}{N_{D n}} e^{q V_{\mathrm{AB}} / k T} \tag{7.44}
\end{equation*}
$$

Looking more carefully at this expression for the diffusion capacitance, we see first that when $V_{A B}$ is negative (i.e., $V_{A B} \ll-k T / q$ ), $C_{d f}$ is essentially zero. This is not surprising because we know that the very little current and excess charge associated with a reverse-biased $p$ - $n$ junction doesn't change much with reverse bias.

For a positive $V_{\mathrm{AB}}$, in contrast, $q_{\mathrm{DF}}$ increases exponentially with bias, as does the current. We can make the connection between $C_{d f}$ and current even clearer if we write $C_{\mathrm{df}}$ directly in terms of the diode current. The diode current in the asymmetrically doped $p^{+}-n$ device we are discussing is essentially all hole current. Thus

$$
\begin{equation*}
i_{D}\left(V_{\mathrm{AB}}\right) \approx I_{D}\left(V_{\mathrm{AB}}\right) \cong A q \frac{n_{i}^{2} D_{h}}{N_{D n}\left(w_{n}-x_{n}\right)} e^{q V_{\mathrm{AB}} / k T} \tag{7.45}
\end{equation*}
$$

where we have assumed that $V_{\mathrm{AB}} \gg k T / q$ so that the 1 in ( $e^{q \nu / k T}-1$ ) can be neglected. Inserting Eq. (7.45) into Eq. (7.42), we find immediately that we can also write $C_{\mathrm{df}}\left(V_{\mathrm{AB}}\right)$ as

$$
C_{\mathrm{df}}\left(V_{\mathrm{AB}}\right)=\frac{\left(w_{n}-x_{n}\right)^{2}}{2 D_{h}} \frac{q}{k T} I_{D}\left(V_{\mathrm{AB}}\right)
$$

The term $\left(w_{n}-x_{n}\right)^{2} / 2 D_{h}$ has units of time and can crudely be identified with the time that the average hole spends diffusing across the $n$-side of the diode. It is
called the transit time $t_{\mathrm{tr}}$. An important and perhaps startling observation is that $C_{\mathrm{df}}$ does not depend on the junction area, only on the total current through it!

If the voltage $\nu_{a b}$ is a function of time, there will be a current into the diode equal to $d q_{\mathrm{df}} / d t$ due to the diffusion capacitance. That is,

$$
\begin{equation*}
i=\frac{d q_{\mathrm{df}}}{d t}=C_{\mathrm{df}} \frac{d v_{\mathrm{ab}}}{d t} \tag{7.46}
\end{equation*}
$$

We will use this result, along with our earlier result for the current into depletion capacitance (Eq. 7.10), when we develop circuit models for $p-n$ diodes.

## Example

Question. Consider a short-base $p^{+}-n$ diode biased at a quiescent current level of 1 mA . Assume that $D_{h}$ is $15 \mathrm{~cm}^{2} / \mathrm{s}$ and that the effective width of the $n$-side of the junction, $w_{n}-x_{n}$, is $1 \mu \mathrm{~m}$. What is the diffusion capacitance per unit area of this junction at room temperature for small-signal operation about this bias point?

Discussion. Using Eq. (7.4b) we calculate $C_{\text {df }} / A$ to be $2.75 \times 10^{-8} \mathrm{~F} / \mathrm{cm}^{2}$, or $0.27 \mathrm{fF} / \mu \mathrm{m}^{2}$. Interestingly, the diffusion capacitance is of the same order of magnitude as the depletion capacitance of the $p^{+}-n$ diode in our earlier example (diode \#1). This is often the case.

### 7.4 CIRCUIT MODELS FOR JUNCTION DIODES

Equation (7.29) describes the current-voltage relationship of an ideal $p-n$ junction diode based on our models for the depletion region and for current flow in the quasineutral regions. We now turn to the problem of developing models for $p-n$ diodes that can be used to analyze circuits incorporating them. We begin with large-signal models and then develop small-signal linear models for $p-n$ diodes.

### 7.4.1 Large-Signal Models

We call a diode with terminal characteristics described by Eq. (7.29) an ideal exponential diode. Specifying the reverse saturation current $I_{S}$ of such a device specifies its terminal characteristics completely. We will use the circuit symbol of Fig. $7.12 a$ for an ideal exponential diode with its current-voltage relationship shown in Fig. 7.12b.

In many situations we will want to use simplified approximations to the ideal exponential diode representation of a $p-n$ diode; in others we will want to use more complicated models that include physical effects and terminal behavior not included in the ideal exponential model. In this section we will look at a variety of large-signal models evolving from this ideal model, beginning with simplified models and then moving to more complex models, including dynamic models.
a) Simplified diode models. In certain applications, even the use of a simple exponential expression like Eq. (7.29) is inconvenient and unnecessarily precise,


FIGURE 7.12
Circuit symbols and current-voltage relationships for three relatively simple large-signal $p-n$ diode models: ( $a$ and $b$ ) the ideal exponential diode; ( $c$ and $d$ ) the ideal diode; ( $e$ and $f$ ) the break-point diode.
and it is desirable to use more approximate but also more readily analyzed models. The simplest is perhaps the ideal diode, which is shown in Fig. 7.12c. The currentvoltage relationship for this device is shown in Fig. 7.12d. Mathematically, this relationship can be described by saying that $i_{D}=0$ when $v_{\mathrm{AB}} \leq 0$ and $v_{\mathrm{AB}}=0$ when $i_{D} \geq 0$.

The ideal diode model for a $p-n$ junction diode ignores the fact that there is some voltage drop across the diode terminals when the diode is forward-biased. In the typical operating range of most silicon diodes, this drop ranges from 0.5 V
to 0.7 V . We will tend to approximate it as 0.6 V in our discussions. This forward "offset" voltage can be incorporated into our model by adding an ideal voltage source to an ideal diode, as shown in Fig. 7.12e. We will call this a break-point diode. Its current-voltage characteristics are shown in Fig. 7.12f.

The decision to use forward offset voltage when approximating the largesignal behavior of a diode must be based on the application at hand. Because the actual diode current increases exponentially with the applied voltage, there is clearly no unambiguous turn-on voltage. At very low currents, a given silicon diode might appear to turn on much below 0.6 V , say at 0.4 V , for example, whereas at very high current levels the turn-on may appear to occur at 0.7 V or more. And if the diode is fabricated from a semiconductor other than silicon, a quite different turn-on voltage may be found. In general, the larger the bandgap of the semiconductor used, the larger the turn-on voltage.

An important feature of these simplified large-signal models for a diode are that they are piecewise linear. They are thus relatively simple to use, which in many instances more than makes up for the lack of precision.
b) Expanded diode models. In some situations, particularly in computer-aided modeling and analysis, the goal is not to use simplified models appropriate for hand calculations, but rather to model as much of the detail of the device performance as possible. We turn now to modeling diodes in this limit.

We saw in Sec. 7.3.3 and Fig. 7.8 that a typical $p-n$ diode behaves like an ideal exponential diode over a part of its range but deviates at low and high current levels. At low current levels the characteristic is still exponential but with a dependence on $q v_{\mathrm{AB}} / n k T$, where $n$ is approximately 2 . This behavior has led to the definition of a generalized exponential diode model, which we say has the following current-voltage relationship:

$$
i_{D}=I_{S}\left(e^{q \nu_{\mathrm{AB}} / n k T}-1\right)
$$

The factor $n$ is called the ideality factor; along with $I_{S}$, it fully specifies any exponential diode. The circuit model of an exponential diode is shown in Fig. 7.13a. Notice that the ideal exponential diode is a special case of the exponential diode model for which $n$ is 1 .

The low-current behavior of a real $p-n$ diode can be modeled as the parallel combination of two exponential diodes, one with an ideality factor $n=1$ and a certain value of saturation current $I_{S}$, and the other with $n=2$ and a somewhat higher saturation current ${ }^{*} I_{S R}$. This is illustrated in Fig. 7.13b. The second diode (the one with $n=2$ ) accounts for generation and recombination in the junc-

[^0]

FIGURE 7.13
Circuit models for a $p$ - $n$ diode, including elements to model the effects not included in the ideal exponential diode model: (a) general exponential diode; $(b)$ two general exponential diodes used in parallel to account for low-level space charge layer recombination; (c) elements included to model high-level injection and series resistance; (d) reverse-breakdown and reverse-bias leakage also included in the model.
tion depletion region. Because the depletion region width varies with the junction voltage, it is common, especially in computer simulation programs such as SPICE, to make $I_{S R}$ vary in a similar fashion with voltage, that is, as $\left(\phi_{b}-v_{J}\right)^{a}$, where $v_{J}$ is the voltage drop across the junction and, for an abrupt $p-n$ junction, $a$ is 0.5 .

The high-current behavior can be accounted for by adding a resistor of resistance $R_{S}$ and a second $n=2$ diode with a much higher saturation current
$I_{\mathrm{KF}}$ in series with this parallel combination of diodes. This is illustrated in Fig. $7.13 c$.

To better model the reverse-bias behavior of a diode, several additional elements can be incorporated into the model. The reverse breakdown of the diode can be modeled by shunting the forward model with another exponential diode connected in opposite polarity relative to the other diodes and in series with a voltage source equal in magnitude to the breakdown voltage. When this is done, a current source $I_{\mathrm{BV}}$ has to be included in parallel with this new exponential diode so that $i_{D}$ will be zero when $v_{\mathrm{AB}}$ is zero. This is shown in Fig. 7.13d. Finally, a resistor of resistance $R_{P}$ can be added in parallel with the exponential diodes to allow for the possibility of parasitic current leakage paths shunting the junction. This element is also included in Fig. 7.13d.
c) Dynamic models with charge stores. The large-signal diode models we have developed thus far do not include any information on charge stores within the device. It is quite appropriate to ignore these charge stores when the terminal voltage on the diode is changing slowly enough that the currents that result from charging and/or discharging the charge stores are negligibly small. However, if the terminal voltages change more rapidly (as occurs during a switching transient or for a high-frequency sinusoidal input signal, for example), then the charging and discharging currents can be substantial and must be accounted for in our modeling. This is traditionally done by adding charge storage elements (i.e., capacitors) to the circuit model in the appropriate places. These capacitors are in general nonlinear; that is, the charge stored on them is a nonlinear function of the voltage difference between their terminals:

In the case of a $p-n$ junction diode, we have two charge stores: the depletion region charge store and the diffusion charge store. The charge-voltage relationship for the depletion region charge store is given, in the case of an abrupt doping profile, by Eq. (7.5):

$$
\begin{equation*}
q_{\mathrm{DP}}\left(v_{\mathrm{AB}}\right)=-A \sqrt{2 \varepsilon q\left(\phi_{b}-v_{\mathrm{AB}}\right) \frac{N_{A P} N_{D n}}{\left(N_{A p}+N_{D n}\right)}} \tag{7.5'}
\end{equation*}
$$

The diffusion charge is described in the case of an abrupt $p^{+}-n$ diode by Eq. (7.41):

$$
\begin{equation*}
q_{\mathrm{DF}}\left(v_{\mathrm{AB}}\right)=q \cdot A \frac{\left(w_{n}-x_{n}\right)}{2} \frac{n_{i}^{2}}{N_{D n}}\left(e^{q v_{\mathrm{AB}} / k T}-1\right) \tag{7.41’}
\end{equation*}
$$

A little thought will show you that these charge stores appear electrically in parallel, so they can be represented by a single nonlinear capacitor. This nonlinear capacitor is in turn parallel with the junction, which we represent by an exponential diode. The resulting circuit model is shown in Fig. 7.14a. Notice that the symbol we use for nonlinear capacitor is the usual symbol for a linear capacitor with a diagonal arrow across it. The arrow implies that the capacitance


FIGURE 7.14
Addition of large-signal, nonlinear charge stores: (a) to a large-signal exponential diode model; (b) to an exponential diode model with series resistance (note that the charge store occurs in parallel with the junction but in series with the diode bulk and the contacts, which together are the source of $R_{S}$ ).
of this capacitor, which we define as $d q / d v$, varies with the voltage across the capacitor.*

The remarks we made in Sec. 7.4.1b about expanding the complexity of our model can be repeated here, and again our understanding of the device physics guides us in placing the additional elements. A common example is accounting for series resistance $R_{S}$. Clearly $R_{S}$ can play an important role in any charging and discharging transients, and it is an obvious parasitic to want to consider. A little thought shows us that $R_{S}$ enters in series with the junction and the charge stores, and thus should be added to the model as illustrated in Fig. 7.14b.

### 7.4.2 Static Small-Signal Linear Models

The large-signal models we developed in the preceding section are needed when analyzing circuit situations in which the terminal voltage and currents can assume

[^1]$$
q_{\mathrm{AB}}=q_{\mathrm{DF}}\left(v_{\mathrm{AB}}\right)+q_{\mathrm{DP}}\left(v_{\mathrm{AB}}\right)
$$
where $q_{\mathrm{DF}}\left(v_{\mathrm{AB}}\right)$ and $q_{\mathrm{DP}}\left(v_{\mathrm{AB}}\right)$ are given by Eqs. (7.41) and (7.5), respectively.
wide ranges of values. Another common type of analysis in which we will be interested concerns small variations in the terminal variables (i.e., the voltage and current) about some reference condition. In such cases it is often the details of the nonlinear characteristic in the vicinity of the reference values that are of primary interest. The reference condition values are termed the quiescent operating point or bias point values, and if the variations about them are small enough the changes in current and voltage will be linearly related.

To proceed, we first set up a notation convention to use in our discussion. We denote the total variable with a lowercase letter and uppercase subscripts. Thus the total diode voltage is $v_{A B}$, and the total diode current is $i_{D}$. We will denote the quiescent portion of these quantities with an uppercase letter with uppercase subscripts. Thus, the quiescent diode voltage is $V_{\mathrm{AB}}$, and the quiescent diode current is $I_{D}$. Any change from the quiescent value is denoted by a lowercase letter with lowercase subscripts (i.e., $\nu_{\mathrm{ab}}$ and $i_{d}$ ) for the present examples. Thus we can write

$$
\begin{equation*}
v_{\mathrm{AB}}=V_{\mathrm{AB}}+v_{\mathrm{ab}} \tag{7.47}
\end{equation*}
$$

and

$$
\begin{equation*}
i_{D}=I_{D}+i_{d} \tag{7.48}
\end{equation*}
$$

We will in general have to determine $V_{\mathrm{AB}}$ and $I_{D}$ using our large-signal models for the characteristics, but ideally, once they are known, we will be able to determine $v_{\mathrm{ab}}$ and $i_{d}$ using linear circuit analysis techniques. Often we will not need to know $V_{\mathrm{AB}}$ and $I_{D}$ with a high degree of accuracy and our simple piecewise linear model, possibly that of Fig. $7.12 e$, will be perfectly adequate. At the same time, we may want to know $\nu_{\mathrm{ab}}$ and $i_{d}$ much more precisely, and having linear models relating them will make it relatively easy to achieve the necessary precision.

Returning now to the device at hand (i.e., the $p-n$ diode), we will first develop a small-signal linear model based on our quasistatic exponential diode model. We will then extend our model for use with high-frequency signals by adding linear capacitors that account for the diffusion and depletion charge stores we identified earlier.
a) Low-frequency models. To relate $v_{a b}$ and $i_{d}$ for a diode, we perform a Taylor's series expansion of $i_{D}$ about $v_{\mathrm{AB}}=V_{\mathrm{AB}}$. We write

$$
\begin{equation*}
i_{D}\left(v_{\mathrm{AB}}\right)=i_{D}\left(V_{\mathrm{AB}}\right)+a_{1}\left(v_{\mathrm{AB}}-V_{\mathrm{AB}}\right)+a_{2}\left(v_{\mathrm{AB}}-V_{\mathrm{AB}}\right)^{2}+\text { Higher-order terms } \tag{7.49a}
\end{equation*}
$$

where $a_{1}$ is $d i_{D} / d v_{\mathrm{AB}}$ evaluated at $V_{\mathrm{AB}}$ and $a_{2}$ is $(1 / 2) d^{2} i_{D} / d v_{\mathrm{AB}}^{2}$ evaluated at $V_{\mathrm{AB}}$. The quantity $i_{D}\left(V_{\mathrm{AB}}\right)$ is $I_{D}$, and using Eqs. (7.47) and (7.48) we have $\left(v_{\mathrm{AB}}-V_{\mathrm{AB}}\right)=v_{\mathrm{ab}}$ and $\left(i_{D}-I_{D}\right)=i_{d}$. Thus, Eq. (7.49a) can be written as

$$
\begin{equation*}
i_{d}=a_{1} v_{\mathrm{ab}}+a_{2} v_{\mathrm{ab}}^{2}+\text { Higher-order terms } \tag{7.49b}
\end{equation*}
$$

We are now in a position to put bounds on $v_{\mathrm{ab}}$ for linear operation. We want to be able to neglect the quadratic and higher-order terms, so we restrict $\left|v_{a b}\right|$ so that the quadratic term is no more than some fraction $f$ of the linear term. Thus we require that

$$
\begin{equation*}
\left|a_{2} v_{\mathrm{ab}}^{2}\right| \leq f\left|a_{1} v_{\mathrm{ab}}\right| \tag{7.50}
\end{equation*}
$$

which thus means that

$$
\begin{equation*}
\left|v_{\mathrm{ab}}\right| \leq f \frac{a_{1}}{a_{2}} \tag{7.51a}
\end{equation*}
$$

If the diode is an ideal exponential diode, then $i_{D}$ and $v_{\mathrm{AB}}$ will be related through Eq. (7.29) and $a_{1}$ and $a_{2}$ are given by

$$
\begin{align*}
& a_{1}=\left.\frac{d i_{D}}{d v_{\mathrm{AB}}}\right|_{v_{\mathrm{AB}}=V_{\mathrm{AB}}}=\frac{q}{k T} I_{s} e^{q V_{\mathrm{AB}} / k T}  \tag{7.52a}\\
& a_{2}=\left.\frac{d^{2} i_{D}}{2 d v_{\mathrm{AB}}^{2}}\right|_{v_{\mathrm{AB}}=V_{\mathrm{AB}}}=\frac{1}{2} \frac{q^{2}}{(k T)^{2}} I_{s} e^{q V_{\mathrm{AB}} / k T} \tag{7.52b}
\end{align*}
$$

Thus we have

$$
\left|v_{\mathrm{ab}}\right| \leq f \frac{a_{1}}{a_{2}}=2 f \frac{k T}{q}
$$

Restricting $v_{\mathrm{ab}}$ to this range, we have our desired linear relationship

$$
\begin{equation*}
i_{d} \approx a_{1} v_{\mathrm{ab}} \tag{7.53}
\end{equation*}
$$

The factor $a_{1}$ has the units of conductance. We usually use the symbol $g_{d}$ for this factor and call it the incremental equivalent diode conductance about the quiescent operating point $\left(I_{D}, V_{\mathrm{AB}}\right)$. In general we have

$$
\begin{equation*}
\left.g_{d} \equiv \frac{d i_{D}}{d v_{\mathrm{AB}}}\right|_{\mathrm{V}_{\mathrm{AB}}} \tag{7.54}
\end{equation*}
$$

This result tells us that incrementally any diode looks like a simple linear conductance $g_{d}$, where the magnitude of this conductance is simply the slope of the diode current-voltage characteristic evaluated at the quiescent operating point. This conclusion is illustrated in Fig. 7.15:

In the special case of an ideal exponential diode, we have

$$
\begin{equation*}
g_{d}=\frac{q}{k T} I_{s} e^{q V_{\mathrm{AB}} / k T} \tag{7.55a}
\end{equation*}
$$

If $V_{\mathrm{AB}}$ is much greater than $k T / q$, then $I_{s} e^{q V_{\mathrm{AB}} / k T}$ is approximately $I_{D}$ and thus we can also write $g_{d}$ as

$$
\begin{equation*}
g_{d} \approx \frac{q I_{D}}{k T} \tag{7.55b}
\end{equation*}
$$

This is the expression that we will usually use to calculate $g_{d}$.

(a)

(b)

FIGURE 7.15
(a) Variation of the current and voltage of a $p-n$ diode about a quiescent operation point ( $I_{D}, V_{\mathrm{AB}}$ ); (b) the corresponding static small-signal equivalent circuit.

## Example

Question. What is the incremental conductance at room temperature of a diode biased at a quiescent current of 1 mA ? If we want $f$ to be 0.1 , what is the restriction on $\left|\nu_{a b}\right|$ ?

Discussion. Using Eq. (7.55b) we calculate that $g_{d}$ is 40 mS ; the corresponding incremental resistance $r_{d}$ (which is $1 / g_{d}$ ) is $25 \Omega$. (Notice that these values do not depend on any of the diode dimensions, doping levels, etc.-only the bias level.)

From Eq. (7.51b), we find that the second-order term will be less than 10 percent of the linear term (i.e., $f=0.1$ ) if $\left|v_{\mathrm{ab}}\right|$ is less than $0.2 \mathrm{kT} / q$, which at room temperature is 5 mV . This doesn't seem like a very large voltage range, but then an exponential is not a very linear function. We will have to see whether this restriction is a problem when we look at applications of junction diodes.

Our notation does not identify the quiescent point explicitly; we simply write $g_{d}$, but it is very important to remember that the value of $g_{d}$ depends directly on the quiescent point parameters.

To summarize our incremental model for the $p-n$ diode, we find that for small variations about a quiescent operating point ( $I_{D}, V_{\mathrm{AB}}$ ), the changes in current and voltage, $i_{d}$ and $v_{\mathrm{ab}}$, respectively, are linearly related by the incremental equivalent diode conductance $g_{d}$, where $g_{d}$ is defined as the slope of the diode characteristic at the quiescent operating point [i.e., Eq. (7.54)]. The fact that these small variations are linearly related is a purely mathematical result that stems from Taylor's


## FIGURE 7.16

Small-signal equivalent circuit of a $p-n$ diode, including the depletion and diffusion capacitances.

Theorem. The physics enters our analysis only when we evaluate the incremental diode conductance $g_{d}$, as we did in Eq. (7.55).
b) Small-signal models for time-varying signals. Our exponential diode expression, Eq. (7.29), and the small-signal equivalent circuit that we derived from it were developed assuming static conditions. This does not restrict us from having some variation of our currents and voltages with time, but it does mean such variations must be "slow." Mathematically, "slow" means that all time derivatives are negligible; physically it means that the carrier and current profiles must be able to respond essentially instantaneously, on the scale of the time variation, to any voltage changes and that any currents supplying or removing charge as the depletion and diffusion charge stores change are negligible. Strictly speaking, if we want to treat rapidly varying situations, we should return to our original equations and include the terms involving time derivatives, but this is a very difficult task. A more manageable and highly successful approach has been to incorporate the charge storage elements that we know must exist in the $p-n$ diode (i.e., the depletion capacitance and diffusion capacitance) and use the resulting hybrid (in a theoretical or modeling sense) model.

Adding the capacitive currents to the exponential diode current, we have

$$
\begin{equation*}
i_{d}=g_{d} v_{\mathrm{ab}}+\left(C_{\mathrm{df}}+C_{\mathrm{dp}}\right) \frac{d v_{\mathrm{ab}}}{d t} \tag{7.56}
\end{equation*}
$$

A circuit representation of this relationship is illustrated in Fig. 7.16.
In Eq. (7.56) and Fig. 7.16, $g_{d}$ is given by Eq. (7.55), $C_{\mathrm{df}}$ by Eq. (7.44), and $C_{\mathrm{dp}}$ by Eq. (7.9). All are clearly functions of the quiescent operating point $\left(I_{D}, V_{\mathrm{AB}}\right)$.

### 7.5 SOLAR CELLS AND PHOTODIODES

Thus far we have considered only voltage excitation of $p-n$ junction diodes. Another important excitation form is light. We consider next optical excitation of $p-n$ diodes and some useful applications of devices operated in this manner.

### 7.5.1 Optical Excitation of $p$ - $n$ Diodes

Consider the $p-n$ diode illustrated in Fig. 7.17, which is illuminated with spatial impulse of light generating $M$ hole-electron pairs $/ \mathrm{cm}^{2} \cdot \mathrm{~s}$ in the plane at $x=x_{L}$. Our objective is to find the diode current as a function of the terminal voltage and the position and intensity of the illumination. For convenience, we denote the diode current as $i_{D}\left(v_{\mathrm{AB}}, M\right)$ to remind us that we have two excitations.

You know enough about $p-n$ junctions and flow problems to solve for $i_{D}\left(v_{\mathrm{AB}}, M\right)$ directly, but it is far more instructive if we use superposition to obtain a solution. We will first calculate the diode current with only the light applied (i.e., with $v_{A B}=0$ ), and then we will calculate the diode current with only the voltage $v_{A B}$ applied (i.e., with no light). We can then add these two currents, $i_{D}(0, M)$ and $i_{D}\left(v_{\mathrm{AB}}, 0\right)$, respectively, to obtain $i_{D}\left(v_{\mathrm{AB}}, M\right)$. We of course, know the second of these current components already; it is just our ideal diode relationship, Eq. (7.29). The problem is to find $i_{D}(0, M)$.

Before proceeding, it is worthwhile to comment about our use of superposition. The flow problems in the quasineutral region are linear problems, and superposition is, of course, a valid technique with them. The boundary conditions at the edges of the depletion region, however, are not linear functions of the junction voltage $v_{A B}$. Thus we must be very careful when separating excitations to make certain that we don't run into problems. Specifically we must make certain that only one portion of our decomposition has a nonzero voltage applied to the junction. Clearly our formulation of the problem meets this requirement.

To calculate $i_{D}(0, M)$, we want to find $J_{e}\left(-x_{p}\right)$ and $J_{h}\left(x_{n}\right)$, add them to get $J_{\mathrm{TOT}}$, and finally multiply by $A$ to get $i_{D}$. We begin by identifying the boundary conditions on the excess carrier populations. Clearly, at the ohmic contacts and at the edges of the depletion region, the excess populations are zero. At $x=x_{L}$, the discontinuity in the slopes of $n^{\prime}(x)$ on either side of $x_{L}$ is $M / D_{h}$. This information is summarized in Fig. 7.18a, where for the sake of convenience we have assumed a very long minority carrier diffusion length. The corresponding minority currents


FIGURE 7.17
A $p-n$ diode illuminated with a spatial impulse generating $M$ hole-electron pairs $/ \mathrm{cm}^{2}$ 's uniformly across the plane at $x=x_{L}$.


FIGURE 7.18
(a) Excess minority carrier distributions in the illuminated $p-n$ diode of

Fig. 7.17; (b) the corresponding minority carrier diffusion current densities on either side of the junction; (c) the complete current density variations throughout the device.
are shown in Fig. 7.18b. The complete current density variations are shown in Fig 7.18c.

A bit of algebra leads us to the result

$$
\begin{equation*}
J_{h}\left(x_{n}\right)=-q M \frac{\left(w_{n}-x_{L}\right)}{\left(w_{n}-x_{n}\right)} \tag{7.57}
\end{equation*}
$$

The electron current $J_{e}\left(-x_{p}\right)$ is zero, so we have

$$
\begin{equation*}
i_{D}(0, M)=-q A M \frac{\left(w_{n}-x_{L}\right)}{\left(w_{n}-x_{n}\right)} \tag{7.58}
\end{equation*}
$$

for $x_{n} \leq x_{L} \leq w_{n}$.
Looking at Fig. 7.18 and Eq. (7.58), we see that the fraction of the optically injected carriers that flow to the depletion region and across the junction result in a diode current. The sign of the current is negative, and its magnitude increases as the illumination moves nearer to the junction.

If the illumination had been on the $p$-side of the junction, we would have found

$$
\begin{equation*}
i_{D}(0, M)=-q A M \frac{\left(w_{p}-x_{L}\right)}{\left(w_{p}-x_{p}\right)} \tag{7.58a}
\end{equation*}
$$

for $-w_{p} \leq x_{L} \leq-x_{p}$.
If the illumination is in the depletion region, all of the injected carriers cross the junction and

$$
\begin{equation*}
i_{D}(0, M)=-q A M \tag{7.58b}
\end{equation*}
$$

for $-x_{p} \leq x_{L} \leq x_{n}$.
In general, then, we can write

$$
\begin{equation*}
i_{D}(0, M)=-q A M f \tag{7.59}
\end{equation*}
$$

where $f$ is a number between 0 and 1 that depends on the position $x_{L}$ of the illumination.

With both light and voltage applied to the diode we have

$$
\begin{equation*}
i_{D}=I_{s}\left(e^{q \nu_{\mathrm{AB}} / k T}-1\right)-I_{L} \tag{7.60}
\end{equation*}
$$

where we have defined $I_{L}$ as the magnitude of the optically generated current - qAMf in our example. This characteristic is plotted in Fig. 7.19.

### 7.5.2 Applications of Illuminated $\boldsymbol{p} \boldsymbol{-} \boldsymbol{n}$ Diodes

Referring to Fig. 7.19, we can identify two important features of the currentvoltage characteristic of an illuminated $p-n$ diode. First, there is a current in reverse bias that is directly proportional to the illumination and is independent of the applied voltage. This effect can be used to sense the presence of light and forms the basis for a device called the photodiode.


FIGURE 7.19
Current-voltage characteristic of an illuminated $p-n$ junction diode.

The second feature is that the diode characteristic now extends into the lower right-hand quadrant of the $i-v$ plane. In this quadrant the device is supplying power; that is, the product of the current into the device times the voltage across its terminals is negative. This observation forms the basis for a device called the solar cell.

We will consider each of these applications in turn below.
a) Photodiodes. The magnitude of the current through a reverse-biased $p-n$ diode that is not illuminated is generally very small. The precise value will, of course, depend on the particular device under consideration, but it will typically be on the order of a few picoamperes or less. When the junction is illuminated this can easily be increased many orders of magnitude to a level well above the background noise. This phenomenon then provides an extremely useful method of sensing the presence of light.

Any $p-n$ junction will be sensitive to light, but several straightforward things can be done with a diode's design to enhance its sensitivity to illumination. Most basically, one should make the junction area large and place the junction near the top surface of the device because, as we know from our discussion of illuminated $p-n$ diodes in Sec. 7.5.1, it is only those photogenerated minority carriers that are able to diffuse to the edge of the space charge region that contribute to the photocurrent. In addition, we should make the top ohmic contact relatively small and place it off to one side, so that it does not block the light from reaching the
junction and does not lead to an excessive amount of recombination. A typical device cross section is shown in Fig. 7.20. The top surface of the device will not in general be an ideal reflecting boundary; rather, it will have a finite surface recombination velocity (see Sec. $5.2 .3 c$ ) and will thus be a source of some loss due to recombination. One way of reducing this is putting a thin, heavily doped region at the surface as illustrated in Fig. 7.20; referring to Fig. 6.8b, you should realize that this creates a potential barrier that tends to keep the minority carriers away from the surface and thereby increases the light sensitivity of the device (i.e., increases the magnitude of the photocurrent obtained for a given light input). Diodes designed in this way specifically to be sensitive to light are called photodiodes.

The amount of photocurrent generated by light depends not only on the intensity of the light but also on the energy of the incident photons. You know from our earlier discussion in Chap. 3 that the energy of the photons must at least exceed the energy gap. On the other hand, if the photons have too much energy they will be absorbed very quickly in the semiconductor and will generate holeelectron pairs very near the surface, where a disproportionately large fraction will recombine. This leads to a drop in the sensitivity of a photodiode at high energies. Thus a photodiode will in general respond only to photons within a limited range of energies; that is, it will respond only to light falling within a limited band of wavelengths. Light of too long a wavelength, or, equivalently, too low an energy, will not generate hole-electron pairs; whereas light of too short a wavelength, that is, of too high an energy, will be absorbed so close to the surface that most of the photogenerated minority carriers will recombine before reaching the space charge layer.

Silicon photodiodes typically respond best to light with a wavelength between 0.7 and 0.9 microns; by taking special care to shield the photogenerated carriers from the surface and by placing the junction very close to the surface, it is possible to extend the range of sensitivity of a Si photodiode to also cover the visible spectrum, 0.4 to $0.7 \mu \mathrm{~m}$, and perhaps even the ultraviolet range of less than $0.4 \mu \mathrm{~m}$. If you want to detect light of longer wavelength (lower en-


FIGURE 7.20
Cross-sectional drawing of a typical silicon photodiode.
ergy), however, silicon is not useful. A semiconductor with a smaller energy gap is needed. Germanium and indium gallium arsenide photodiodes, for example, are well suited for use in the near-infrared region around $1.5 \mu \mathrm{~m}$, and mercury cadmium telluride photodiodes can be designed to respond to wavelengths of anywhere from 2 to $20 \mu \mathrm{~m}$, depending on the relative amounts of mercury and cadmium in them.

Photodiodes are extensively used as light sensors in many different applications, and you very likely encounter them daily, often without realizing it. The sensor for the remote control on a television set or VCR is a photodiode, for example; so is the sensor for the laser scanner at the supermarket checkout counter. The light meter in a camera very likely also uses a photodiode, and when you call home for money, there is a good possibility that the signal carrying your conversation is sent as light over an optical fiber and converted back to an electrical signal by a photodiode.

For some applications a simple photodiode like that pictured in Fig. 7.20 is not fast enough or sensitive enough. In such situations more sophisticated device designs are required. One alternative design is to place an undoped (i.e., intrinsic) layer between the $p$ - and $n$-type sides of the junction. The resulting $p-i-n$ structure has a relatively wide, uniform electric field across the $i$-region. A large fraction of the light in a $p-i-n$ photodiode is absorbed in the depletion region, and the photogenerated carriers are quickly swept (drifted) across the junction. The structure is both sensitive and fast. Yet another photodiode design is the avalanche photodiode. This device is designed to be operated with a reverse bias just at the edge of avalanche breakdown (see Sec. 7.3.3c). Photogenerated carriers crossing the junction then will create additional hole-electron pairs through the avalanche process. Each photon thus creates many carriers; that is, there is gain, whereas in the other photodiodes we have discussed each photon leads to at most one carrier crossing the junction. Avalanche photodiodes are particularly useful where very high sensitivity is required.
b) Solar cells. A solar cell is a simple $p-n$ junction photodiode designed so that its spectral response is well suited to illumination by sunlight. It is operated so that there is net electrical power output from its terminals. The most important characteristics of a solar cell are how efficiently it converts input solar energy to electrical energy and, in most applications, how much it costs. As might be expected, there are trade-offs between cost and efficiency. Silicon solar cells are by far the most prevalent. They are relatively inexpensive and can reach efficiencies on the order of 10 percent. The spectral response of gallium arsenide solar cells is a somewhat better match to the solar spectrum than that of silicon, and they can achieve efficiencies of 25 percent, but they cost considerably more. On the other extreme, thin-film (polycrystalline or amorphous) silicon solar cells can be made very cheaply because they do not involve high-quality single-crystal material, but for the same reason they are relatively inefficient (only a few percent). Many light-powered pocket calculators rely on such thin-film silicon solar cells.

### 7.6 LIGHT-EMITTING DIODES

In a forward-biased long-base $p$ - $n$ diode, all of the excess minority carriers injected into either side of the junction recombine with majority carriers in the quasineutral regions (refer to Fig. 7.7c). In silicon diodes, each hole-electron pair that recombines releases an amount of energy equivalent to the energy gap (i.e., approximately 1.1 eV ) and does so primarily in the form of thermal-energy phonons (i.e., heat). In other semiconductors such as gallium arsenide, an appreciable fraction of this recombination energy is released as optical-energy photons (i.e., light). A forward-biased long-base GaAs diode will thus generate an appreciable amount of light. If the diode is configured and packaged so that it forms a useful source of light, it is called a light-emitting diode (LED). Getting the light out is actually a rather difficult problem. The light is emitted in random directions, but because of the large index of refraction of GaAs ( $n \approx 3.5$ ) it must intersect the surface of the device within $15^{\circ}$ of the normal or it will suffer total internal reflection and never get out. (It will eventually be absorbed.) The usual solution is to keep the junction close to the top surface to minimize the absorption before the light reaches the top surface the first time, and to package the device in a hemisphere-shaped high-refractive-index plastic dome. The diode is typically a rectangular chip 250 to 300 microns on a side, with the junction near the top surface; the dome will be several millimeters in diameter, as pictured in Fig. 7.21a. The high refractive index of the plastic increases the critical angle at the semiconductor-plastic interface, considerably increasing the fraction of the light able to exit the semiconductor. Once the light enters the plastic it will intersect the surface of the dome at near normal incidence and most of it will exit.


FIGURE 7.21
(a) Sketch of a typical light-emitting diode chip and its package; (b) the emission spectrum of a GaAs LED.

The energy gap of GaAs is about 1.4 eV , and GaAs LEDs emit in a narrow band at about $0.9 \mu \mathrm{~m}$, as shown in Fig. 7.21b. Our eyes are not very sensitive at this wavelength, so we cannot see this emission, but it is very well matched to silicon photodiodes (see Sec. 7.5.2a). The light source in the remote control on a VCR is probably a GaAs LED.

The red, amber, and green light-emitting diodes in the dashboards of many cars are made from semiconductors with wider energy gaps than gallium arsenide. Many red and amber LEDs are made of gallium arsenide phosphide. The ratio of arsenic to phosphorus in the semiconductor crystal used to make the device determines the color. Green LEDs and some red LEDs are made of gallium phosphide. In this case it is the dopant that determines the color. Nitrogen doping yields green emission, whereas doping with zinc and oxygen yields red. The details of how this works are not difficult to understand but are beyond the scope of this text.

To date there are no efficient blue LEDs, but there is a great deal of research effort being expended in an effort to make them. In the infrared direction there are a variety of materials that can be used to make light-emitting diodes operating out as far as 30 microns, though most applications are much nearer to 1 micron.

Finally, it is significant that hole-electron recombination can be optically stimulated, that is, that a photon passing a conduction electron can catalyze the recombination of that electron with a hole, causing it to emit another photon traveling in the same direction as (and in phase with) the original photon. If there is a very large population of excess conduction electrons and a large population of excess holes, then this process can lead to a veritable avalanche of coherent photons, and with the addition of a suitable optical resonant cavity a laser can be formed. The excess populations can be created at a forward-biased p-n junction, and the cavity can be formed by suitably cutting the semiconductor crystal. The details are complex and again beyond the scope of this text, but the basic concept is quite straightforward, and laser diodes are extremely useful devices. Most compact disc players, for example, use laser diode light sources to interrogate the discs. Most optical fiber communication systems also use laser diode sources.

### 7.7 SUMMARY

In this chapter we have seen that we can develop a model for the current-voltage relationship of a $p-n$ junction diode by envisioning the diode as being composed of three regions: two quasineutral regions and a depletion, or space charge, region. We looked at current flow in quasineutral regions in Chap. 5 and unbiased depletion regions in Chap. 6. In this chapter we have extended our depletion region model to include bias by arguing first that all of the applied voltage appears across the depletion region, reducing the potential barrier there; the depletion approximation remains a valid model for the net charge, electric field, and electrostatic potential in the depletion region. We have also argued that the majority carrier populations remain essentially in thermal equilibrium with the potential barrier at the junction; this gave us a way of determining boundary conditions on the excess minority carrier concentrations on either side of the junction. Finally, we
have argued that except for a small amount of generation or recombination in the depletion region, the hole and electron currents are continuous across the depletion region; this gave us a way of determining the total diode current. With these assumptions we obtained

$$
i_{D}=I_{S}\left(e^{q v_{\mathrm{AB}} /(k T)}-1\right)
$$

with $I_{S}$ given by

$$
I_{S}=A q n_{i}^{2}\left(\frac{D_{e}}{N_{A p} w_{p}^{*}}+\frac{D_{h}}{N_{D n} w_{n}^{*}}\right)
$$

where $w_{p}^{*}$ and $w_{n}^{*}$ are given by

$$
\begin{aligned}
& w_{p}^{*} \equiv L_{e} \tanh \left(\frac{w_{p}-x_{p}}{L_{e}}\right) \\
& w_{n}^{*} \equiv L_{h} \tanh \left(\frac{w_{n}-x_{n}}{L_{h}}\right)
\end{aligned}
$$

Looking at these expressions we have seen that the diode current can become very large in forward bias, whereas it saturates at a very small value in reverse bias. We have also seen that the current across an asymmetrically doped junction tends to be dominated by carriers from the more heavily doped side. Furthermore, for two otherwise similar diodes with the same voltages applied, the more lightly doped diode has more current.

We have seen that there are limitations in our model, particularly at very low and very high current levels as well as at very large reverse biases. We have shown how our ideal exponential diode model could be extended to incorporate effects not considered in our basic model, as well as how it could be simplified to obtain a model useful for hand calculations. One of the important things you will want to develop as you use these models to analyze circuits is an appreciation of when a simple model can be used and when it is necessary to use a more complicated model.

We have also shown that there is charge storage associated with a $p-n$ junction and have introduced the concepts of depletion and diffusion capacitance. The amount of stored charge in each of these charge stores was seen to be a nonlinear function of the diode voltage.

We have discussed linear equivalent circuit models for $p-n$ diodes valid for small-signal operation about a bias point. We have shown that at low frequencies a diode looks incrementally like a resistor whose value $k T / q I_{D}$ depends on the bias current level $I_{D}$. To extend this model to higher frequencies, we have defined two small-signal capacitances, the depletion capacitance and the diffusion capacitance, to model the two junction charge stores in small-signal linear equivalent circuit analyses.

Finally, we have considered the interaction of light with $p-n$ diodes. We have seen that an illuminated $p-n$ diode can convert optical energy to electrical energy and can serve as a useful power source and light detector. We have also seen that $p-n$ diodes fabricated in certain materials emit light when forward-biased
because a large fraction of the accompanying hole-electron recombination occurs via radiative processes. These red, yellow, and green light emitters can be found in many modern electronic gadgets.

## PROBLEMS

7.1 Consider an abrupt silicon $p-n$ junction with $N_{p}=5 \times 10^{17} \mathrm{~cm}^{-3}$ and $N_{n}=$ $10^{16} \mathrm{~cm}^{-3}$ at room temperature:
(a) Find the numerical value for the ratio of the depletion region width on the $n$-side, $x_{n}$, to the width on the $p$-side, $x_{p}$.
(b) Find the total width of the depletion layer (in microns).
(c) Find the maximum electric field $\mathscr{E}_{\max }$ in this junction for applied biases of (i) $V_{A}=0$ and (ii) $V_{A}=-12 \mathrm{~V}$.
(d) The breakdown electric field in moderately doped silicon is approximately $5 \times 10^{5}$ $\mathrm{V} / \mathrm{cm}$. At what reverse bias will $\mathscr{E}_{\text {max }}=5 \times 10^{5} \mathrm{~V} / \mathrm{cm}$, and what will the depletion region width be at that bias?
7.2 A certain silicon $p-n$ junction is known to have the doping profile illustrated in Fig. P7.2. Note: $\left.N_{\Pi}^{\prime} x\right) \equiv N_{d}(x)-N_{a}(x)$. Assume that this device is at room temperature, $n_{i}=10^{10} \mathrm{~cm}^{-3}, k T / q=0.025 \mathrm{~V}$, and $\varepsilon_{\mathrm{si}}=10^{-12} \mathrm{~F} / \mathrm{cm}$. The cross-sectional area is $2.5 \mathrm{~cm}^{2}$. Use the depletion approximation to arrive at your answers.
(a) What is the thermal equilibrium electrostatic potential relative to intrinsic silicon far to the left and right of the junction (i.e., for $x \gg 0$ and for $x \ll 0$ )?
(b) For a certain applied bias the width of the depletion region on the $n$-side, $x_{n}$, is $2 \mu \mathrm{~m}$. What is the corresponding depletion region width on the $p$-side, $x_{p}$ ?


FIGURE P7.2


FIGURE P7.3
7.3 Consider the $p^{+}-n-n^{+}$diode pictured in Fig. P7.3.

Use the depletion approximation to answer this question.
(a) At what bias level $\nu_{\mathrm{AB}}$ is the $n$-region fully depleted?
(b) (i) Find an expression for the depletion region width as a function of $v_{A B}$ when $v_{\mathrm{AB}}$ is negative and $\left|v_{\mathrm{AB}}\right|$ is greater than the value you found in part a (i.e., when the depletion region extends into the $n^{+}$region).
(ii) Find an expression for the peak electric field in the same bias range.
(c) If the critical electrical field for breakdown is $5 \times 10^{5} \mathrm{~V} / \mathrm{cm}$ in Si with $n_{0}=$ $10^{16} \mathrm{~cm}^{-3}$, what is the maximum voltage that can be applied to this device before it breaks down?
(d) Compare your answer in part c to the breakdown voltage of a comparable $p^{+}$. $n$ diode (i.e., one with a long $n$-region rather than the $n^{+}$-region). Does the presence of the $n^{+}$-region increase or decrease the breakdown voltage? Can you explain your answer?
7.4 This problem concerns the design of a voltage adjustable resistor like that pictured in Fig P7.4. This device is simply a diffused resistor like the one you designed in Problem 3.4 with a heavily doped $p$-region added over the conducting channel that thins it and increases its resistance. By varying the reverse bias between the $p$ - and $n$-regions we vary the width of the conducting channel and thus adjust the resistance of the diffused resistor.
In your design you may assume that the $n$-region is uniformly doped. Also assume that the voltage drop in the resistor is small, so that it is essentially all at the same potential for purposes of calculating the junction depletion widths. Select the dimensions of the device and doping level of the $n$-region subject to the constraints that the minimum line width, $W$, is $2 \mu \mathrm{~m}$; the final thickness of the $n$-region, $T$, must fall between 1 and $4 \mu \mathrm{~m}$; and the doping of the $n$-region should be between $10^{15} \mathrm{~cm}^{-3}$ and $10^{18} \mathrm{~cm}^{-3}$. You want to design a device that meets the specifications given in part a below that has the smallest possible capacitance between terminals 2 and 1.
(a) Design a device that will have a resistance of $1 \mathrm{k} \Omega$ with $\nu_{21}=-.5 \mathrm{~V}$ and a resistance of $2 \mathrm{k} \Omega$ with $v_{21}=-10 \mathrm{~V}$.
(b) Plot the resistance (at low $v_{31}$ ) versus $v_{21}$ of the device you have designed over what you feel is the useful operating range. Explain why you have chosen this operating range.
(c) Discuss qualitatively how the resistance of your device changes as $v_{31}$ becomes large (i.e., on the order of a volt or more). You should find looking ahead to the discussion in Sec. 10.2 useful in this regard.


## FIGURE P7.4

7.5 The data from a measurement of the small-signal capacitance of a silicon $p^{+}-n$ diode structure as a function of bias voltage is plotted in the form $1 / C_{d p}^{2}$ versus $v_{\mathrm{AB}}$ in Fig. P7.5. The area of the junction is $10^{-3} \mathrm{~cm}^{2}$. Use this data to answer the following questions about the device.
(a) What is the built-in potential of this junction?
(b) What is the doping level of the more lightly doped side ( $n$-side) of this diode in the vicinity of the junction? Note that in a $p^{+}-n$ junction, $N_{A p} \gg N_{D n}$ and we can write $N_{A p} N_{D n} /\left(N_{A p}+N_{D n}\right) \cong N_{D n}$, so Eq. (7.9b) can be simplified somewhat.


FIGURE P7.5
(c) What is the doping level of the more heavily doped side? Hint: Use your knowledge of $\phi_{0}$ and $N_{D n}$.
(d) At some distance from the junction the doping level changes.
(i) At what distance from the junction does the change occur?
(ii) Does the doping level increase or decrease at this point, and what does it become?
(e) Suppose that in addition to the above structure there is a very heavily doped $n^{+}$-region $3 \mu \mathrm{~m}$ from junction. How would you expect the plot of $1 / C_{d p}^{2}$ versus $V_{A B}$ to look in this case? Sketch and explain your answer.
7.6 Consider two abrupt silicon $p-n$ diodes with identical dimensions, carrier mobilities, and minority carrier diffusion lengths that differ in terms of doping. In diode A, $N_{n}=10^{16} \mathrm{~cm}^{-3}$ and $N_{p}=10^{17} \mathrm{~cm}^{-3}$; in diode B, $N_{n}=10^{17} \mathrm{~cm}^{-3}$ and $N_{p}=$ $10^{18} \mathrm{~cm}^{-3}$.
(a) With the same reverse bias applied to each diode, which of these diodes has the largest depletion capacitance and why?
(b) With the same forward current flowing in each diode, which of these diodes has the larger diffusion capacitance and why?
(c) With the same forward voltage bias applied to each diode, which of these diodes has the larger diffusion capacitance and why?
(d) Which of these diodes has the largest reverse breakdown voltage and why?
7.7 Consider a $p-n$ diode with the following dimensions and doping levels:

$$
\begin{aligned}
n \text {-side }: & N_{D_{n}}=5 \times 10^{17} \mathrm{~cm}^{-3} \\
& w_{n}=1 \mu \mathrm{~m} \\
& \tau_{h}=10^{-6} \mathrm{~s} \\
p \text {-side }: & N_{A p}=10^{16} \mathrm{~cm}^{-3} \\
& w_{p}=4 \mu \mathrm{~m} \\
& \tau_{e}=10^{-5} \mathrm{~s}
\end{aligned}
$$

This diode is fabricated in silicon for which $\mu_{e}=1600 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}, \mu_{h}=600 \mathrm{~cm}^{2} / \mathrm{V}$. s , and $n_{i}=1.0 \times 10^{10} \mathrm{~cm}^{-3}$ at room temperature. The cross-sectional area of this device is $10^{-4} \mathrm{~cm}^{2}$.
(a) Can this diode be modeled using either the long- or short-base approximation? Which one, if either, and why?
(b) What is $I_{S}$ in the expression for the diode current, that is, in the relation $i_{D}=$ $I_{S}\left(e^{q \nu_{\mathrm{AB}} / k T}-1\right) ?$
(c) When this diode is forward-biased, what fraction of the total current is holes flowing from the $p$ - to the $n$-side? Which fraction is electrons going from $n$ to $p$ ?
(d) What is the built-in potential of this junction?
(e) At what bias level does the low-level injection assumption start to be violated, assuming that LLI is valid as long as $n^{\prime}$ and $p^{\prime}$ are less than 10 percent of the majority carrier population?
(f) Is LLI violated first on the $n$-side or on the $p$-side, or does violation occur simultaneously on both?
(g) (i) What is the diode current density at the bias point of part e?
(ii) What are the resistive voltage drops in the quasineutral regions at this bias level?
(h) Plot the excess electron concentration on the $p$-side of this diode on a linear scale for the following bias conditions:
(i) 0.2 V forward bias, $v_{\mathrm{AB}}=+0.2 \mathrm{~V}$
(ii) 1.0 V reverse bias, $v_{\mathrm{AB}}=-1.0 \mathrm{~V}$
(i) How would your plots in (ii) of part h change if $v_{\mathrm{AB}}$ was -5.0 V ?
7.8 Consider the three diodes shown in Fig. P7.8. All have the same cross-sectional area $A$, and all contacts are ohmic. Carrier mobilities are as follows:

$$
\begin{aligned}
N_{A} \text { or } N_{D}=10^{17} / \mathrm{cm}^{3}: \mu_{e} & =600 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{~s} \\
\mu_{h} & =250 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{~s} \\
N_{D}=10^{15} / \mathrm{cm}^{3}: \mu_{e} & =1300 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{~s} \\
\mu_{h} & =350 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{~s}
\end{aligned}
$$

The minority carrier lifetime in the $p$-type material is $10^{-8} \mathrm{~s}$. In the $n$-type material the minority carrier lifetime is $4 \times 10^{-7} \mathrm{~s}$ for $N_{D}=10^{15} / \mathrm{cm}^{3}$ and $5 \times 10^{-8} \mathrm{~s}$ for $N_{D}=10^{17} / \mathrm{cm}^{3}$. Assume the depletion region widths can be ignored.


FIGURE 97.8
(a) For each diode find the numerical ratio of the hole current to the electron current at the junction.
(b) Find the numerical ratio of the total junction current in diode I to that in diode II, and find the numerical ratio of the current in II to that in III, assuming that the diodes are operated at the same voltage.
(c) Diodes I and II are connected in parallel across a forward-bias voltage source $v_{D}=0.25 \mathrm{~V}$. What fraction of the total current goes through diode I?
(d) Diodes II and III are connected in series so that both conduct in forward bias when connected to a voltage source $v_{D}=1 \mathrm{~V}$. What fraction of the total voltage appears across diode II?
(e) A forward-bias voltage $v_{D}=0.36\left(=k T / q \ln 10^{6}\right)$ is applied to diode I. Make labeled sketches showing how the following quantities vary throughout the diode: $p^{\prime}(x), n^{\prime}(x), J_{h}(x), J_{e}(x)$.
7.9 In Problem 6.4 you analyzed a linearly graded junction. Now consider applying bias to this same junction. Assume that $\phi_{0}$ is known and that a reverse bias $v_{A}<0$ is applied to the junction. From your expression in (i) of part $b$ of that problem show that $w\left(v_{A}\right)$ varies as the cube root of $\left(\phi_{b}-v_{A}\right)$.
7.10 The short-circuited, symmetrically doped $p-n$ diode shown in Fig. P7.10 is illuminated by a distributed source that generates $g_{L}=g_{0} \sin (\pi x / w)$ hole-electron pairs $/ \mathrm{cm}^{3} \cdot$ s in the region of $0 \leq x \leq w$. Assume the following: low-level injection; $w_{p}=w_{n}=w ; w \ll L_{h}, w \ll L_{e} ; \mu_{e}=4 \mu_{h} ; N_{a}=N_{d}$.

Make labeled sketches of the following over the range $-w_{p} \leq x \leq w_{n}$.
(a) $n^{\prime}(x)$
(b) $J_{e}(x)$
(c) $J_{h}(x)$
(d) Find the total short-circuit current of the diode.
7.11 Design an instrument that uses the semiconductor bar shown in Fig. P7.11, with two $p-n$ junctions, as part of an accurate position sensor. Although the structure resembles


FIGURE P7. 10


FIGURE P7.11
an $n-p-n$ bipolar transistor, both junctions are reverse-biased during operation. The way it works is that a spot of light hits the $p$-region of the sample at position $x_{L}$. and the two currents $i_{1}$ and $i_{2}$ are measured. From these two values, the instrument should calculate the value of $x_{L}$. The two junctions are a distance $2 W$ apart, and for convenience the origin is taken to be midway between the two junctions. Consider only current flow in the $x$-direction.
(a) Neglect recombination in the $p$-region. Find $i_{1}$ and $i_{2}$ as functions of $x_{L}$ and the number of electron-hole pairs generated per unit time, $M$. You may restrict $x_{L}$ to be between $-W$ and $W$.
(b) Because the light source generating the illumination has an intensity that cannot be controlled accurately, you have to design the logic in the instrument to find $x_{L}$ independent of $M$. What equation can you use? (Continue to neglect recombination in the $p$-region.)
(c) During production of the instrument, one shipment of semiconductor bars was suspected of having high recombination in the $p$-region. You have asked the quality control engineer to measure $i_{2}$ versus $x_{L}$; before he returns, you calculate the expected curve for a high-recombination case, where the electron diffusion length in the $p$-region is W/5. Plot your calculated curve.
7.12 It has been discovered that hole-electron pair recombination in $n$-type nitrogen-doped gallium phosphide, GaP , is predominantly radiative, emitting green light. A certain device designer wants to make green GaP light-emitting diodes and has the following materials available to use in his design:

$$
\begin{aligned}
& n \text {-type, } \mathrm{N}_{2} \text {-doped, } N_{D}=10^{18} \mathrm{~cm}^{-3} \\
& n \text {-type, } \mathrm{N}_{2} \text {-doped, } N_{D}=5 \times 10^{16} \mathrm{~cm}^{-3} \\
& p \text {-type, } \mathrm{Zn} \text {-doped, } N_{A}=10^{18} \mathrm{~cm}^{-3} \\
& p \text {-type, } \mathrm{Zn} \text {-doped, } N_{A}=5 \times 10^{16} \mathrm{~cm}^{-3}
\end{aligned}
$$

In each instance, $D_{e}=25 \mathrm{~cm}^{2} / \mathrm{s}, D_{h}=5 \mathrm{~cm}^{2} / \mathrm{s}$, and $\tau=10^{-6} \mathrm{~s}$.
(a) Which is the best combination of materials to use to make an efficient green light-emitting $p-n$ junction diode? Explain your answer.
(b) In a GaP green LED, we want the holes injected into the $n$-side to recombine in the semiconductor and not at the ohmic contact. Thus the $n$-side should be much wider than a minority carrier diffusion length. How wide, $w_{n}$, should the $n$ -
side be to ensure that less than 10 percent of the injected carriers recombine at the contact? GaP is costly, so find a lower limit for the width $w_{n}$. Use reasonable approximations.
(c) When designing this device, is it better to select the width of the $p$-side so that it operates in the long-base limit or short-base limit, or does it matter? Explain your answer.
(d) Consider for the sake of argument a GaP LED that is sufficiently thick that it operates in the long-base limit on both sides of the junction; that is, $\left|w_{p}\right| \gg$ $L_{e},\left|w_{n}\right| \gg L_{h}$. Assume also that the device is doped as you said it would be in part a above. When the diode is forward-biased, what fraction of the total current is carried by electrons at the following positions in the device and why:
(i) In the depletion region at the junction?
(ii) Inside the semiconductor close to the ohmic contact on the $p$-side?
(iii) Inside the semiconductor close to the ohmic contact on the $n$-side?
7.13 Consider the $p^{+}-n$ diode illustrated in Fig. P7.13. The $n$-side of this diode is relatively lightly doped ( $10^{16} \mathrm{~cm}^{-3}$ ) over the half of its thickness nearest the junction and is more heavily doped ( $10^{17} \mathrm{~cm}^{-3}$ ) over the portion nearest the contact. Assume that the low-level injection assumption is valid for the purposes of this question and that the minority carrier diffusion lengths are much greater than $w_{p}$ and $w_{n}$ (i.e., that the infinite lifetime assumption is valid).
(a) (i) Find the electrostatic potential step $\Delta \phi$ between the lightly doped $n$-region $\left(0<x<w_{n} / 2\right)$ and the more heavily doped $n^{+}$-region $\left(w_{n} / 2<x<w_{n}\right)$.
(ii) Sketch the electrostatic potential in the vicinity of $x=w_{n} / 2$.
(b) (i) Find the equilibrium minority carrier population in the $n$ - and $n^{+}$-regions.
(ii) Find an expression for the ratio of the equilibrium minority carrier population in the $n$-region to that in the $n^{+}$-region in terms of $\Delta \phi$.
(c) Assume now that the diode is forward-biased and that excess minority carriers (holes) are injected into the $n$-side of the junction.
(i) Use your result in (ii) of part b above to relate the total population of holes just to the right of $w_{n} / 2$ to that just to the left of $w_{n} / 2$, assuming that the hole population stays in quasiequilibrium with the potential step at $w_{n} / 2$, [i.e., maintains the ratio that you found in (ii) of part b].
(ii) Assuming that the excess minority carrier population $p^{\prime}(x)$ substantially exceeds the equilibrium minority carrier population $p_{o}(x)$, find a relationship between the excess population of holes just to the right of $w_{n} / 2$ and that just to the left of $w_{n} / 2$.
(iii) Sketch the excess minority carrier population $p^{\prime}(x)$ between the edge of the depletion region $x_{n}$ and the ohmic contact at $w_{n}$. The excess minority


FIGURE P7. 13
carrier population at the edge of the depletion region on the $n$-side of the junction is $n_{i}^{2}\left(e^{q \nu_{A B}} / k T-1\right) / N_{D n}$. Also remember that the minority carrier diffusion length is much greater than $w_{n}$. You should assume that $x_{n}$ is much less than $w_{n}$.
(d) Find an expression for the current through this diode, $i_{D}$, as a function of the applied voltage $v_{\mathrm{AB}}$.
(e) Compare your answer in part d to what you would have obtained if the $n$-side of this diode was uniformly doped. Use this comparison to find the "effective width" of the $n$-side of the original diode, where we define the effective width as the width the $n$-side would have to have in a diode with a uniformly doped $n$-side and the same hole current density. (Note: The effective width you find should be much greater than $w_{n}$.)
7.14 Consider the abrupt, symmetrically doped silicon $p$ - $n$ diode with a $n^{+}$-region next to the $n$-side contact as illustrated in Fig. P7.14. The net doping level on either side of the junction is $5 \times 10^{16} \mathrm{~cm}^{-3}$, and the doping level in the $n^{+}$-region is $10^{18} \mathrm{~cm}^{-3}$. The electron and hole mobilities, $\mu_{e}$ and $\mu_{h}$, are $1600 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}$ and $640 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}$, respectively, and the minority carrier lifetime throughout the device is $10^{-6} \mathrm{~s}$. The instrinsic carrier concentration $n_{i}$ is $10^{10} \mathrm{~cm}^{-3}$. Assume $k T / q$ is 0.025 V .
(a) What is the built-in potential at the $p-n$ junction in this device?
(b) Sketch and dimension the electrostatic potential as a function of position in this device for $x$ between $-5 \mu \mathrm{~m}$ and $+11 \mu \mathrm{~m}$. Do not calculate any depletion region widths.
(c) Assume now that the diode is illuminated by light that creates $10^{20}$ hole-electron pairs $/ \mathrm{cm}^{2} \cdot \mathrm{~s}$ uniformly across the plane at $x=-5 \mu \mathrm{~m}$.
(i) Sketch the excess minority carrier concentration profile as a function of position throughout the device with this illumination.
(ii) What is the short-circuit current through the illuminated diode? Give an answer accurate to $\pm 5 \%$.
(d) Repeat (i) and (ii) of part c, assuming that the illumination is now across the plane at $x=+5 \mu \mathrm{~m}$ rather than at $-5 \mu \mathrm{~m}$.


FIGURE P7.14

## CHAPTER 8

## BIPOLAR JUNCTION TRANSISTORS

Having completed our modeling of the p-n junction diode, we now turn our attention to the bipolar junction transistor, or BJT. There are two types of BJTs, $p n p$ and $n p n$, one structure being simply an $n$-for- $p$ and $p$-for- $n$ transformation of the other. We will initially focus our attention on the npn BJT. After that, treating the pnp BJT will be straightforward.

An example of what an $n p n$ bipolar junction transistor might look like is illustrated in Fig. 8.1. The working "heart" of the device is the portion directly beneath contact E , the emitter contact, and extending to the back contact C , the collector contact. Contact B represents the base contact. This portion of the device is illustrated in Fig. 8.2. This is the structure that we will analyze in this chapter to develop a model for the terminal characteristics of the BJT. Before doing so, however, we will first try to understand qualitatively how this device works.

The BJT can be thought of in several ways. One way is to regard it as two closely spaced and interacting $p-n$ junctions which is basically how our model in this chapter will present it. One of these junctions, the base-collector junction, is reverse-biased, and its current (the collector current) would normally be negligibly small. In the BJT, however, this junction is very near the second junction, the emitter-base junction. If the emitter-base junction is forward-biased, electrons will be injected across it from the emitter into the base and toward the base-collector junction; the result will be a collector current because these electrons will readily flow across the reverse-biased base-collector junction. Furthermore, the size of this collector current will depend directly on the number of electrons emitted into the base (i.e., on the emitter current), which in turn depends directly on the emitter-base voltage. We thus view the collector current as being controlled by the emitter-base voltage and as being proportional to the emitter current or, equally


FIGURE 8.1
Cross section of a rudimentary npn bipolar transistor fabricated in silicon using a so-called planar process.
well, to the base current (which is the difference between the emitter and collector currents).

Another way to think about an $n p n$ BJT is as two $n$-type semiconductor regions separated by a $p$-type barrier. A positive bias is applied between one of the $n$-regions, the emitter, and the other, the collector, so that electrons in the emitter are attracted to the collector. No current flows, though, because the intervening p-region, the base, blocks the electrons. However, by applying a second bias between the first $n$-region (the emitter) and the $p$-region (the base), the potential barrier to electron flow presented by the base region can be reduced and a current will flow. If things are done correctly, a small change in the base-to-emitter voltage will lead to a large change in the current flowing from the emitter to the collector and the transistor will have appreciable gain. In the bipolar transistor we make electrical contact directly to the middle, current-blocking region of the device and we vary the potential of that region relative to the outer regions directly. Later


FIGURE 8.2
Quasi-one-dimensional bipolar transistor structure to be used in modeling the device in Fig. 8.1.
(in Chap. 10) we will see another type of device, the field effect transistor, in which we will make capacitive contact to the blocking region. After discussing that device it will be interesting to compare and contrast these two devices.

In this chapter we will begin with a quantitative model for the static relationships between the terminal voltages and currents in the bipolar junction transistor; the model we will develop is called the Ebers-Moll model. After discussing this model and its limitations, we will develop several large-signal circuit models for bipolar junction transistors, including models for time-varying signals. We will also develop a variety of linear circuit models for BJTs suitable for describing the response of this device to small-signal variations about a quiescent operating point. The models we develop will vary widely in their complexity and in the assumptions we make in deriving them; one of our goals will be to understand which model to use when. We will conclude this chapter with a look at optically excited BJTs, devices we call phototransistors.

### 8.1 THE EBERS-MOLL MODEL FOR UNIFORMLY DOPED ONE-DIMENSIONAL <br> BJTS

The heart of the BJT illustrated in Fig. 8.1 is the region under the emitter contact, which can to a large extent be modeled as a quasi-one-dimensional transistor like that illustrated in Fig. 8.2.* The device is composed of three uniformly doped regions - the emitter, base, and collector-with, respectively, doping levels $N_{D E}, N_{A B}$ and $N_{D C}$ and widths $w_{E}, w_{B}$, and $w_{C}$, as illustrated in Fig. 8.2. Note that we have added a subscript $E, B$, or $C$ to indicate that we are dealing with the emitter, base, or collector, respectively. We will also add such a subscript (an $E$, $B$, or $C$ ) to certain other parameters to denote to which region they pertain. For example, $D_{e B}$ is the electron diffusion constant in the base. Finally, the minority carrier diffusion length in each region is assumed to be much greater than the effective width of that region (e.g., $L_{h E} \gg w_{E}^{*}$ ).

We apply arbitrary voltages $v_{B E}$ and $v_{B C}$ to the terminals of the device and ask what the currents $i_{E}$ and $i_{C}$ are. That is, we want to determine $i_{E}\left(v_{B E}, v_{B C}\right)$ and $i_{C}\left(v_{B E}, v_{B C}\right)$. Note that the third current, $i_{B}$, is not independent of these two; that is, $i_{B}$ is $-\left(i_{E}+i_{C}\right)$. Similarly, the third voltage, $v_{C E}$, is also not independent; that is, $v_{C E}$ is $-\left(v_{B C}-v_{B E}\right)$.

### 8.1.1 Superposition

It is possible, and not even particularly difficult, to solve this problem directly. Once $\nu_{B E}$ and $\nu_{B C}$ are specified, all of the boundary conditions are known and

[^2]the corresponding flow problems are all well defined and solvable. However, a much greater understanding of the BJT is obtained if we first break the problem into two pieces by applying one voltage at a time, solve for the resulting currents, and then use superposition to combine the two solutions into the total solution. We thus divide the problem into a "forward" portion in which $v_{B E}$ is applied, with $v_{B C}$ set to zero; and a "reverse" portion in which $v_{B C}$ is applied and $v_{B E}$ is zero.

You should be a bit uncomfortable at this point because we are talking of using superposition in a problem that contains various nonlinearities. To begin with, the boundary conditions are nonlinear functions (exponential) of the junction voltages. Each junction has only one nonzero voltage applied to it, however, so this nonlinearity never becomes an issue and superposition is applicable. A more serious nonlinearity is the dependence of the space charge layer widths and, consequently, the dependence of the quasineutral region widths on the junction voltages. We avoid this problem for now by assuming that we can neglect the space charge layer widths relative to $w_{E}^{*}, w_{B}^{*}$, and $w_{C}^{*}$ and thus that the quasineutral region widths are unchanged with changing junction bias (i.e., are not functions of $v_{B E}$ and $v_{B C}$ ). We will return to this point in Sec. 8.1.5 and discuss how to design a device to ensure that this is a good assumption. We also will see how the device characteristics are affected when this assumption begins to break down.

### 8.1.2 The Forward Portion ( $v_{B C}=0$ )

In the forward problem, we have $v_{B C}=0$ and want to obtain $i_{E}\left(v_{B E}, 0\right)$, which we label $i_{E F}$, and $i_{C}\left(v_{B E}, 0\right)$, which we label $i_{C F}$. The excess minority carrier populations on either side of the base-collector junction are zero because $\nu_{B C}=0$. We denote this as $n^{\prime}\left(w_{B}^{-}\right)=0$ and $p^{\prime}\left(w_{B}^{+}\right)=0$, where the + and - superscripts indicate the space charge layer edges on either side of the junction. Furthermore, the excess populations at $x=-w_{E}$ and at $x=w_{B}+w_{C}$ are zero because of the ohmic contacts on the emitter and collector, respectively.

At the emitter-base junction the excess populations are set by $v_{E B}$. They are

$$
\begin{align*}
& p^{\prime}\left(0^{-}\right)=\frac{n_{i}^{2}}{N_{D E}}\left(e^{q \nu_{B E} / k T}-1\right)  \tag{8.1}\\
& n^{\prime}\left(0^{+}\right)=\frac{n_{i}^{2}}{N_{A B}}\left(e^{q \nu_{B E} / k T}-1\right) \tag{8,2}
\end{align*}
$$

Because $L_{h E} \gg w_{E}, L_{e B} \gg w_{B}$, and $L_{h C} \gg w_{C}$, we know that the excess minority carrier profiles in the transistor are linear and must look as shown in Fig. 8.3. We can immediately write an expression for the emitter current:

$$
\begin{equation*}
i_{E F}=-q A\left[\frac{D_{h} p^{\prime}\left(0^{-}\right)}{w_{E}^{*}}+\frac{D_{e} n^{\prime}\left(0^{+}\right)}{w_{B}^{*}}\right] \tag{8.3}
\end{equation*}
$$

where $A$ is the cross-sectional area of the junction. Using Eqs. (8.1) and (8.2), this becomes

$$
\begin{equation*}
i_{E F}=-q A n_{i}^{2}\left(\frac{D_{h}}{N_{D E} w_{E}^{*}}+\frac{D_{e}}{N_{A B} w_{B}^{*}}\right)\left(e^{q v_{B E} / k T}-1\right) \tag{8.4}
\end{equation*}
$$



FIGURE 8.3
Excess minority carrier profiles for the device of Fig. 8.2 with $v_{B E}>0$ and $v_{B C}=0$.

This current consists of holes flowing from the base into the emitter (the first term in the first parentheses) and electrons flowing from the emitter into the base (the second term). That is,

$$
\begin{equation*}
i_{E F}=i_{F h}+i_{F e} \tag{8.5a}
\end{equation*}
$$

The emitter electron current $i_{F e}$ is the most important component of the emitter current in npn transistors, and we will focus our attention on it. Referring to Eq. (8.4) we see that $i_{F e}$ can be written as

$$
\begin{equation*}
i_{F e}=-q A n_{i}^{2} \frac{D_{e}}{N_{A B} w_{B}^{*}}\left(e^{q v_{B E} / k T}-1\right) \tag{8.6}
\end{equation*}
$$

Using this we can write

$$
\begin{equation*}
i_{E F}=i_{F e}\left(1+\delta_{E}\right) \tag{8.5b}
\end{equation*}
$$

where $\delta_{E}$, defined as $i_{F h} / i_{F e}$, is called the emitter defect. From Eq. (8.4) we see that

$$
\begin{equation*}
\delta_{E}=\frac{D_{h} N_{A B} w_{B}^{*}}{D_{e} N_{D E} w_{E}^{*}} \tag{8.7}
\end{equation*}
$$

Some of the electrons in $i_{F e}$ recombine with holes in the base, but the vast majority flow across the base and out the collector. Thus, the collector current can be written as

$$
\begin{equation*}
i_{C F}=-i_{F e}\left(1-\delta_{B}\right) \tag{8.8}
\end{equation*}
$$

where $\delta_{B}$ represents the fraction of the electrons entering at the emitter that recombine in the base. The term $\delta_{B}$ is called the base defect. The product $\delta_{B} i_{F e}$ is the base recombination current, which we will write as $i_{B r}$.

To calculate $\delta_{B}$ we note that the recombination occurring on any plane $x$ in the base is $A n^{\prime}(x) / \tau_{e B}$ where $\tau_{e B}$ is the minority carrier lifetime in the base. The total recombination in the base is thus the integral of this quantity from $0^{+}$to $w_{B}^{-}$. Multiplying this integral by $-q$ yields the base recombination current $i_{B r}$ :

$$
\begin{equation*}
i_{B r}=-q \int_{0^{+}}^{w_{B}^{-}} \frac{A n^{\prime}(x)}{\tau_{e B}} d x \tag{8.9a}
\end{equation*}
$$

or, because $A$ and $\tau_{e B}$ are constants,

$$
\begin{equation*}
i_{B r}=-\frac{q A}{\tau_{e B}} \int_{0^{+}}^{w_{B}^{-}} n^{\prime}(x) d x \tag{8.9b}
\end{equation*}
$$

Because the excess carrier profile is triangular, this integral is easy to evaluate. We find by inspection that it is $n^{\prime}\left(0^{+}\right) w_{B}^{*} / 2$, and that

$$
\begin{equation*}
i_{B r} \approx-\frac{q A n^{\prime}\left(0^{+}\right) w_{B}^{*}}{2 \tau_{e B}} \tag{8.9c}
\end{equation*}
$$

Recognizing that $i_{F e}=-q A D_{e B} n^{\prime}\left(0^{+}\right) / w_{B}^{*}$ [see Eqs. (8.3) and (8.5a)] we can write

$$
\begin{equation*}
i_{B r}=\frac{w_{B}^{* 2}}{2 D_{e B} \tau_{e B}} i_{F e} \tag{8.10}
\end{equation*}
$$

Thus, because $i_{B r}=\delta_{B} i_{F e}$, we immediately have

$$
\begin{equation*}
\delta_{B}=\frac{w_{B}^{* 2}}{2 D_{e B} \tau_{e B}} \tag{8.11a}
\end{equation*}
$$

which can also be written as

$$
\begin{equation*}
\delta_{B}=\frac{w_{B}^{* 2}}{2 L_{e B}^{2}} \tag{8.11b}
\end{equation*}
$$

Returning to the terminal currents, we first rewrite Eq. (8.4) as

$$
\begin{equation*}
i_{E F}=-I_{E S}\left(e^{q v_{B E} / k T}-1\right) \tag{8.12a}
\end{equation*}
$$

where we have defined $I_{E S}$, the emitter-base diode saturation current, as

$$
\begin{equation*}
I_{E S} \equiv q A n_{i}^{2}\left(D_{h} / N_{D E} w_{E}^{*}+D_{e} / N_{A B} w_{B}^{*}\right) \tag{8.12b}
\end{equation*}
$$

Using Eqs. (8.12) in Eq. (8.6), we find we can write $i_{F e}$ in terms of $i_{E F}$ and $I_{E S}$ as

$$
i_{F e}=\frac{i_{E F}}{\left(1+\delta_{E}\right)}=\frac{-I_{E S}}{\left(1+\delta_{E}\right)}\left(e^{q \nu_{B E} / k T}-1\right)
$$

Combining this result with Eq. (8.8) yields

$$
\begin{equation*}
i_{C F}=-\left(\frac{1-\delta_{B}}{1+\delta_{E}}\right) i_{E F}=\frac{\left(1-\delta_{B}\right)}{\left(1+\delta_{E}\right)} I_{E S}\left(e^{q \nu_{B E} / k T}-1\right) \tag{8.13a}
\end{equation*}
$$

We will write this as

$$
\begin{equation*}
i_{C F}=-\alpha_{F} i_{E F}=\alpha_{F} I_{E S}\left(e^{q \nu_{B E} / k T}-1\right) \tag{8.13b}
\end{equation*}
$$

where we have defined $\alpha_{F}$, the forward alpha, as

$$
\begin{equation*}
\alpha_{F} \equiv \frac{\left(1-\delta_{B}\right)}{\left(1+\delta_{E}\right)} \tag{8.14}
\end{equation*}
$$

Note that $\alpha_{F}$ will be very near to 1 if $\delta_{E}$ and $\delta_{B}$ are small, but it will always be less than 1 .

The third current, the forward portion base current $i_{B F}$, is given by

$$
\begin{equation*}
i_{B F}=-i_{E F}-i_{C F} \tag{8.15a}
\end{equation*}
$$

Using Eqs. (8.6) and (8.8), this can be written as

$$
\begin{equation*}
i_{B F}=-i_{F e}\left(\delta_{E}+\delta_{B}\right) \tag{8.15b}
\end{equation*}
$$

At this point we should consider what these results mean. The three equations we want to examine are Eqs. $(8.6),(8.8)$, and $(8.15 b)$, which we collect here:

$$
\begin{gather*}
i_{E F}=i_{F e}\left(1+\delta_{E}\right)  \tag{8.6}\\
i_{C F}=-i_{F e}\left(1-\delta_{B}\right)  \tag{8.8}\\
i_{B F}=-i_{F e}\left(\delta_{E}+\delta_{B}\right) \tag{8.15b}
\end{gather*}
$$

The emitter current is made up of electrons flowing from the emitter into the base region, $i_{F e}$, and holes flowing from base into the emitter. Equation (8.6) focuses our attention on the emitter electron current, because the electrons are what can lead to collector current. The hole current is "lost," so it is desirable to keep $\delta_{E}$ small. The collector current is the emitter electron current less the electrons that recombine in the base. Clearly we also want to keep $\delta_{B}$ small.

The base current is composed of the holes forming the hole portion of the emitter current, $i_{F h}=-\delta_{E} i_{F e}$, and the holes recombining with electrons in the base, $i_{B r}=-\delta_{B} i_{F e}$. By making $\delta_{E}$ and $\delta_{B}$ small, we keep the magnitude of $i_{B F}$ small relative to $i_{C F}$ and $i_{E F}$.

All of the terminal currents and their various components are represented in Fig. 8.4. You may wish to refer to it and review the preceding discussion before proceeding.

We often write the collector current in terms of the base current and view the base current as the signal, or control, current. We see from Eqs. (8.8) and (8.15b) that $i_{C F}$ and $i_{B F}$ are proportional, and we call the factor of proportionality the forward beta, $\beta_{F}$. We write

$$
\begin{equation*}
\beta_{F} \equiv \frac{i_{C F}}{i_{B F}} \tag{8.16}
\end{equation*}
$$

which we see from Eqs. (8.8) and (8.15b) can be written as

$$
\begin{equation*}
\beta_{F}=\frac{\left(1-\delta_{B}\right)}{\left(\delta_{E}+\delta_{B}\right)} \tag{8.17a}
\end{equation*}
$$



FIGURE 8.4
Schematic representation of the current flux components in an npn bipolar transistor with $v_{B E}>0$ and $v_{B C}=0$.
$\beta_{F}$ is related to $\alpha_{F}$ as

$$
\begin{equation*}
\beta_{F}=\frac{\alpha_{F}}{\left(1-\alpha_{F}\right)} \tag{8.17b}
\end{equation*}
$$

Conversely,

$$
\begin{equation*}
\alpha_{F}=\frac{\beta_{F}}{\left(\beta_{F}+1\right)} \tag{8.17c}
\end{equation*}
$$

We note from Eq. (8.17a) that if $\delta_{E}$ and $\delta_{B}$ are small, $\beta_{F}$ will be large. This is, of course, entirely consistent with Eq. (8.17b) and our earlier observation that $\alpha_{F}$ is very near 1 if $\delta_{E}$ and $\delta_{B}$ are small.

Summarizing, for the forward portion of the transistor characteristics, we have

$$
i_{E F}=-I_{E S}\left(e^{q v_{B E} / k T}-1\right) \equiv-i_{F}
$$

and

$$
\begin{equation*}
i_{C F}=-\alpha_{F} i_{E F}=\alpha_{F} i_{F} \tag{8.13a'}
\end{equation*}
$$

with

$$
\begin{equation*}
I_{E S}=q A n_{i}^{2}\left(\frac{D_{h}}{N_{D E} w_{E}^{*}}+\frac{D_{e}}{N_{A B} w_{B}^{*}}\right) \tag{8.18}
\end{equation*}
$$

A circuit model that has the same terminal characteristics is illustrated in Fig. 8.5. The diode in this circuit is an ideal exponential diode.

### 8.1.3 The Reverse Portion ( $v_{B E}=0$ )

In the reverse portion of our decomposition of the general terminal characteristics of the BJT, we have $\nu_{B E}=0$ and are looking for $i_{E}\left(0, v_{B C}\right) \equiv i_{E R}$ and


FIGURE 8.5
Circuit representation of the terminal characteristics of an npn bipolar transistor with $v_{B E}$ applied and $v_{B C}=0$.
$i_{C}\left(0, v_{B C}\right) \equiv i_{C R}$. The treatment is exactly analogous to that followed in the forward portion. We find that

$$
\begin{equation*}
i_{C R}=-q A n_{i}^{2}\left(\frac{D_{h}}{N_{D C} w_{C}^{*}}+\frac{D_{e}}{N_{A B} w_{B}^{*}}\right)\left(e^{q v_{B C} / k T}-1\right) \tag{8.19a}
\end{equation*}
$$

Writing this as

$$
\begin{equation*}
i_{C R}=i_{R h}+i_{R e} \tag{8.19b}
\end{equation*}
$$

we define a collector defect $\delta_{C}$, as

$$
\begin{equation*}
\delta_{C} \equiv \frac{i_{R h}}{i_{R e}} \tag{8.20a}
\end{equation*}
$$

From Eq. (8.19a),

$$
\begin{equation*}
\delta_{C}=\frac{D_{h} N_{A B} w_{B}^{*}}{D_{e} N_{D C} w_{C}^{*}} \tag{8.20b}
\end{equation*}
$$

Using Eq. (8.20a) we can write

$$
\begin{equation*}
i_{C R}=i_{R e}\left(1+\delta_{C}\right) \tag{8.21}
\end{equation*}
$$

Also, we find that

$$
\begin{equation*}
i_{E R}=-i_{R e}\left(1-\delta_{B}\right) \tag{8.22}
\end{equation*}
$$

where the base defect $\delta_{B}$ is the same as that defined in Eq. (8.11).
We define a reverse alpha $\alpha_{R}$ as

$$
\begin{equation*}
\alpha_{R} \equiv-\frac{i_{E R}}{i_{C R}} \tag{8.23}
\end{equation*}
$$

which, using Eqs. (8.21) and (8.22), is

$$
\begin{equation*}
\alpha_{R}=\frac{\left(1-\delta_{B}\right)}{\left(1+\delta_{C}\right)} \tag{8.24}
\end{equation*}
$$

We can also define a reverse beta $\beta_{R}$ as

$$
\begin{equation*}
\beta_{R} \equiv \frac{i_{E R}}{i_{B R}} \tag{8.25a}
\end{equation*}
$$

which can be written as

$$
\begin{equation*}
\beta_{R}=\frac{\left(1-\delta_{B}\right)}{\left(\delta_{C}+\delta_{B}\right)} \tag{8.25b}
\end{equation*}
$$

or, using Eq. (8.24), as

$$
\begin{equation*}
\beta_{R}=\frac{\alpha_{R}}{\left(1-\alpha_{R}\right)} \tag{8.25c}
\end{equation*}
$$

To summarize the reverse portion terminal currents, we have

$$
\begin{equation*}
i_{C R}=-I_{C S}\left(e^{q v_{B C} / k T}-1\right) \tag{8.26}
\end{equation*}
$$

with

$$
\begin{equation*}
I_{C S}=q A n_{i}^{2}\left[\frac{D_{h}}{N_{D C} w_{C}^{*}}+\frac{D_{e}}{N_{A B} w_{B}^{*}}\right] \tag{8.27}
\end{equation*}
$$

and

$$
\begin{equation*}
i_{E R}=-\alpha_{R} i_{C R}=\alpha_{R} i_{R}=\alpha_{R} I_{C S}\left(e^{q v_{B C} / k T}-1\right) \tag{8.28}
\end{equation*}
$$

An equivalent circuit for the reverse portion is shown in Fig. 8.6. Notice in this figure that for convenience we have defined a new current $i_{R}$, which we have taken to be $-i_{C R}$.

### 8.1.4. Full Solution: The Ebers-Moll Model

Having solved for the current-voltage relationships at the terminals, first with only $v_{B E}$ applied and then with only $v_{B C}$ applied, we are now ready to use superposition to obtain the terminal characteristics when both $v_{B E}$ and $v_{B C}$ are implied. We simply add the currents to get

$$
i_{E}=i_{E F}+i_{E R}
$$

Using Eqs. (8.12) and (8.28) we arrive at

$$
\begin{equation*}
i_{E}\left(v_{B E}, v_{B C}\right)=-I_{E S}\left(e^{q v_{B E} / k T}-1\right)+\alpha_{R} I_{C S}\left(e^{q v_{B C} / k T}-1\right) \tag{8.29a}
\end{equation*}
$$

Similarly,

$$
i_{C}=i_{C F}+i_{C R}
$$



FIGURE 8.6
Circuit representation of the terminal characteristics of an npn bipolar transistor with $v_{B C}$ applied and $v_{B E}=0$.


FIGURE 8.7
Circuit representation of the Ebers-Moll model equations for the npn bipolar transistor.
which, using Eqs. (8.13) and (8.26), is

$$
\begin{equation*}
i_{C}\left(v_{B E}, v_{B C}\right)=\alpha_{F} I_{E S}\left(e^{q \nu_{B E} / k T}-1\right)-I_{C S}\left(e^{q \nu_{B C} / k T}-1\right) \tag{8.29b}
\end{equation*}
$$

Equations (8.29a) and (8.29b) represent the Ebers-Moll model for the bipolar junction transistor. The circuit representation is shown in Fig. 8.7. This circuit is often referred to as the Ebers-Moll model of the bipolar transistor, although, of course, the model also includes the assumptions and approximations that went into developing it.

The four parameters in the Ebers-Moll model are not all independent. Using our earlier expressions it is easy to show that

$$
\begin{equation*}
\alpha_{F} I_{E S}=\alpha_{R} I_{C S} \tag{8.30}
\end{equation*}
$$

That this be true is required by reciprocity, one of the properties of realizable systems.

### 8.1.5 Characteristics and Operating Regions

Now that we have obtained expressions for the terminal characteristics of a BJT, we should see what these characteristics look like and consider what they can teach us about how best to use this device. The BJT is a three-terminal device. We usually view it as a two-port network that has one terminal in common with both the input and output ports. We did this when we derived the Ebers-Moll model, for example; we took the base to be the common terminal, but we also could have selected the emitter or collector, although the latter is of little interest. We will look in this section at characteristics for two modes of operation, common-base and common-emitter.

We also have choices to make with respect to the terminal variables (i.e., currents and voltages). We must choose which variables will be dependent and which will be independent. In the Ebers-Moll model, for example, we took the emitter and collector currents to be dependent on the base-emitter and base-collector voltages. We will consider other possibilities below.
a) Common-base operation. In the Ebers-Moll model the base terminal was common to both the forward and reverse portions. We thus speak of this model as a common-base configuration, and we will look at the terminal characteristics for this mode of operation first.

Consider first the collector current. The Ebers-Moll expressions tell us that it is composed of two components: the base-collector exponential diode current and a fraction of the emitter-base exponential diode current. These two components are plotted as a function of the base-collector voltage $v_{B C}$ and for several values of $v_{B E}$ in Figs. $8.8 a$ and $b$, respectively. The total collector current is the sum of these two components and is plotted in Fig. $8.8 c$. This plot represents the


FIGURE 8.8
Common-base output characteristics of an npn BJT: (a) the base-collector exponential diode characteristic; ( $b$ ) the collector current due to the base-emitter diode current for several values of $v_{B E}$ chosen to give linear increments in $i_{E}$; (c) the total collector current.
common-base output characteristic because the base terminal is common to both of the voltage parameters, $v_{B C}$ and $v_{B E}$, and because the collector terminal is commonly thought of as the output terminal, whereas in this case the emitter terminal is viewed as the input terminal.

We indicated above that the families of curves in Fig. 8.8 were created by varying $v_{B E}$, which strictly speaking is true. However, it makes much more sense to think of varying $i_{E}$ to create a family because $i_{C}$ depends linearly on $i_{E}$ over a substantial range (i.e., $i_{C} \approx-\alpha_{F} i_{E}$ when $v_{B C}<0$ ). In contrast, $i_{E}$, and thus $i_{C}$, depend exponentially on $v_{B E}$, and exponential dependences are awkward to work with; it is much easier to deal with linear variations. Thus families of curves such as those in Fig. 8.8 c are presented with $i_{E}$ rather than $v_{B E}$ as the input parameter. Mathematically, we think in terms of $i_{C}\left(i_{E}, v_{B C}\right)$, rather than $i_{C}\left(v_{B E}, v_{B C}\right)$.

The common-base input characteristic (i.e., $i_{E}$ versus $\nu_{B E}$, with $i_{C}$ or $v_{B C}$ as a parameter) is identical in shape to the output characteristic. It does, however, differ quantitatively to the extent that $I_{E S}$ and $I_{C S}$, and $\alpha_{F}$ and $\alpha_{R}$ differ in magnitude. Examples of both characteristics are illustrated in Figs. 8.9a and $b$. (Notice that the horizontal axes are $-v_{B E}$ and $-v_{B C}$. This differs from Fig. 8.8 and is a more common way of plotting these curves.)

Although the common-base input and output characteristics look similar, it is important to realize that we normally operate BJTs using different regions on each characteristic. That is, we normally operate with the emitter-base junction forward-biased ( $v_{B E}>0$ ) in the present npn example and with the base-collector junction reverse-biased $\left(v_{B C}<0\right)$. Thus we operate in the first quadrant of the output characteristics, Fig. $8.9 b$, and in the third quadrant of the input characteristics, Fig. 8.9a. Notice that for input characteristics we do not change the independent variables from $v_{B E}$ and $v_{B C}$ to $v_{B E}$ and $i_{C}$. Because we usually use the BJT with the base-collector junction reverse-biased, $i_{C}$ is very small and has less meaning


FIGURE 8.9
Input and output families of common-base characteristics for a BJT: (a) the input family; (b) the output family. (The nornal operating region in each set of characteristics is indicated by the solid curves.)
than $v_{B C}$, which is useful for calculating the base-collector junction depletion capacitance.* In any event, the input characteristic of a good device is essentially independent of the output variable, whether $i_{C}$ or $v_{B C}$.

In summary, to operate the BJT in the common-base mode, we first establish an emitter diode current $i_{E}$ by adjusting the input voltage $v_{B E}$; the output current $i_{C}$ will then essentially match this input current independent of the output voltage $v_{B C}$ as long as the base-collector junction is kept reverse-biased. In this operating region, the output current tracks the input current.

Note that we could also consider operating this device with the emitter-base junction reverse-biased and the collector-base junction forward-biased, in which case the collector would be used as the input and the emitter as the output (i.e., $i E \approx-\alpha_{R} i_{C}$ ). However, as we shall see in Sec. 8.1.6, $\alpha_{F}$ is usually much closer to 1 than $\alpha_{R}$ is, so this alternative biasing arrangement is clearly less attractive.
b) Common-emitter operation. A second important mode of operating a BJT is common-emitter operation, for which the output is taken from the collector-emitter pair and the input is applied to the base. If we use the Ebers-Moll expressions to calculate the common-emitter characteristics, we obtain the plots shown in Fig. 8.10. The input family of characteristics is $i_{B}$ as a function of $v_{B E}$ and $v_{C E}$, and the output family is $i_{C}$ as a function of $i_{B}$ and $v_{C E}$. The voltage applied to the base can also be considered the input control signal, but the best choice for the output control parameter is the base current $i_{B}$. This is so because when $v_{C E}$ is more than a few tenths of a volt positive, $i_{C}$ is essentially $\beta_{F} i_{B}$, and when it is negative, $i_{C}$ is $-\left(\beta_{R}+1\right) i_{B}$. These dependences are indicated in Fig. 8.10.

There are several different regions for the output characteristics of Fig. $8.10 b$. First, there are the active regions, which are the regions where the output currents are proportional to $i_{B}$. The forward active region corresponds to operation with the base-emitter junction forward-biased so that the base current is positive and with the collector-emitter voltage a few tenths of a volt positive (in which case the base-collector junction is reverse-biased). This region corresponds to the first quadrant where $i_{C} \approx \beta_{F} i_{B}$, independent of $v_{C E}$. The reverse active region corresponds to operation in the third quadrant where $i_{C}$ is $-\left(\beta_{R}+1\right) i_{B}$, or equivalently, $i_{E} \approx \beta_{R} i_{B}$. In this region, the collector-emitter voltage is a few tenths of a volt or more negative and the base-collector junction is forward-biased, so the base current is again positive and the emitter-base is reverse-biased. Of these two active regions, the forward active region is the one normally used. As we shall see in Sec. 8.1.6, BJTs are usually designed to optimize their performance in this region.

[^3]

FIGURE 8.10
Common-emitter characteristics, with the various regions of operation indicated: (a) input family (the dashed curve shows a representative input curve for $v_{C E}$ negative); (b) output family.

The input characteristics for a BJT biased in the forward active region (see Fig. 8.10a) are those of the base-emitter diode and are largely independent of $v_{C E}$, as long as $v_{C E}$ is greater than a few tenths of a volt positive. This corresponds to having the base-collector junction either reverse-biased or at least not sufficiently forward-biased to be conducting. (Notice that the bias across the base-collector junction, $v_{B C}$, is the base-emitter voltage $v_{B E}$ minus $v_{C E}$, so even a small positive $v_{C E}$ is enough to ensure that the base-collector junction is off.)

Another important region on the BJT characteristics is where $i_{B}$ is zero or negative (in an npn device). This region is called cutoff and corresponds to the portion of the characteristics in Fig. $8.10 b$ along the horizontal axis where $i_{C}$ and $i_{E}$ are extremely small. In this region both junctions are either reverse-biased or not sufficiently forward-biased to be turned on.

Finally, the region on the BJT characteristics in the vicinity of the vertical axis where it is no longer true that the output current is proportional to $i_{B}$ and independent of $v_{C E}$ is called the saturation region. In this region both of the junctions in the BJT are forward biased. They need not be forward-biased to an extent that they strongly conduct, but they must be forward-biased enough that they conduct somewhat (e.g., 0.4 V in silicon devices).

The cutoff and saturation regions often represent the limits of operating a BJT as a switch (an application we will study in Chap. 15). A cutoff BJT looks at its output like an open switch; a saturated BJT looks like a closed switch. If, on the other hand, we want to use a BJT as a linear amplifier (the topic of Chaps. 11 through 14), we will operate it in the forward active region. We seldom operate in the reverse active region because $\beta_{R}$ is typically much smaller than $\beta_{F}$ in a well-designed BJT.

TABLE 8.1
Tabulation of the four possible combinations of bias conditions of the two junctions in a BJT and the operating regions to which they correspond.

| Emitter-base junction | Base-collector junction | Operating region |
| :--- | :--- | :--- |
| Reverse bias | Reverse bias | Cutoff |
| Forward bias | Reverse bias | Forward active |
| Reverse bias | Forward bias | Reverse active |
| Forward bias | Forward bias | Saturation |

The various operating regions of a BJT differ, as we have stressed, in the bias state of the two junction diodes. A convenient way of summarizing our discussion, then, is to make a small chart of all of the possible combinations of forward and reverse biases on the junctions and identify each combination with an operating region. This is illustrated in Table 8.1.

Another useful way to solidify our understanding of the operating regions is to sketch the excess minority carrier profiles through a BJT biased in each of the four regions. An example of such a set of plots is shown in Fig. 8.11. In addition to helping you visualize what is happening in the device in each of the four regions and developing your BJT intuition, these plots will also have practical significance when we discuss how quickly transistors can be switched from one operating region to another (as we shall do in Chap. 16). The excess charge distributions change a great deal in going from one region of operation to another, and the charge making up these excess distributions has to be supplied or removed in the process of switching. The amount of charge that has to be supplied or removed will determine how quickly the switching will occur.

### 8.1.6 Basic Transistor Design

We now turn our attention to what the Ebers-Moll model can teach about designing a better transistor. Consider first the defects we defined in developing that model. Judging from their names, one would guess that it is desirable to keep the defects, $\delta_{E}, \delta_{B}$, and $\delta_{C}$, small when designing a bipolar transistor. We will see now that we can indeed structure a device to keep $\delta_{E}$ and $\delta_{B}$ small, but we will also see that we obtain better device characteristics if we don't insist on making $\delta_{C}$ small.

The base defect $\delta_{B}$ [Eq. (8.11a)] will be small if $w_{B}$ is much less than $L_{h B}$, which was actually one of our initial assumptions. As a consequence of this requirement, BJTs are constructed with narrow base regions, that is, with $w_{B}$ from 0.1 to $1.0 \mu \mathrm{~m}$. One limit on making $w_{B}$ small is the lateral resistance of this layer. Recall that we have neglected any voltage drop due to the base current flowing in from the side (see Fig. 8.1). In very thin-base devices, this voltage drop may no longer be negligible when the base current becomes large, which can severely limit the operation of the BJT at high current levels. Another limit on $w_{B}$ is our assumption that the junction depletion widths and their variation with


FIGURE 8.11
Minority carrier profiles through a BJT biased in (a) cutoff, (b) the forward active region, (c) the reverse active region, and (d) saturation. (It is assumed that the doping level in the base is one-fifth of that in the emitter and twice that in the collector. The same forward bias level is assumed in all cases.)
$v_{E B}$ and $v_{C B}$ are negligible with respect to $w_{B}$. The smaller the value of $w_{B}$, the weaker this assumption.

The emitter defect $\delta_{E}[\mathrm{Eq}$. (8.7)] depends on many parameters, but the most important are the emitter and base doping levels. Clearly it is desirable to have $N_{D E}$ much greater than $N_{A B}$, so silicon BJTs are fabricated with the emitter much more heavily doped than the base. The device designer has less flexibility in the other factors that affect $\delta_{E}$. The ratio of $D_{h}$ to $D_{e}$ is set by the material; in fact, in an $n p n$ it is less than 1 , which is one reason to favor an $n p n$ over a pnp. The ratio of $w_{B}^{*}$ to $w_{E}^{*}$ is restricted to be in the range of 2 to 5 , typically, because of the practical problems of fabricating a device with a thick $w_{E}$ and of keeping $L_{h}$ large in heavily doped material.

The collector defect $\delta_{C}$ [Eq. (8.20b)] is a function similar to $\delta_{E}$. It can be made small by making $N_{D C}$ much greater than $N_{A B}$, but this leads to a problem. BJTs normally operate with the base-collector junction reverse-biased, but the depletion region increases with reverse bias, primarily into the lightly doped side
of a junction (i.e., into the base if $N_{A B}<N_{D C}$ ). This is very undesirable because it leads to an effective base width $w_{B}^{*}$ that is very sensitive to $v_{B C}$. In extreme cases, the depletion region will reach completely through the base, leading to a condition called punch-through, effectively a short-circuiting of the collector to the emitter. In order to avoid these problems, it is necessary to make $N_{A B}$ much greater than $N_{D C}$.

With $N_{A B}$ much greater than $N_{D C}, \delta_{C}$ will be large and thus $\beta_{R}$ will be small (in fact, less than 1). A bipolar transistor designed in accordance with these guidelines clearly has an asymmetry and a preferred operating direction. That is, such a transistor is designed to operate with the emitter-base junction forwardbiased and the base-collector junction reversed-biased, resulting in a large forward current gain $\beta_{F}$ and a collector current that is insensitive to $\nu_{B C}$. Both of these are very desirable features for BJTs designed for use in linear amplifiers and other analog circuits.

Some device designers do not think in terms of the defects that we have defined here; instead they use a closely related set of parameters. For example, instead of the emitter defect $\delta_{E}$, we can equivalently speak of the emitter efficiency $\gamma_{E}$, which is defined as the ratio of the current flowing from the emitter into the base, $i_{F e}$ in an $n p n$, to the total emitter current, $i_{E F}$ :

$$
\begin{equation*}
\gamma_{E} \equiv \frac{i_{F e}}{i_{E F}} \tag{8.31a}
\end{equation*}
$$

This can be written in terms of $\delta_{E}$ using Eq. (8.6).

$$
\begin{equation*}
\gamma_{E}=\frac{1}{1+\delta_{E}} \tag{8.31b}
\end{equation*}
$$

Clearly if we want the emitter defect $\delta_{E}$ to be as small as possible, we also want the emitter efficiency $\gamma_{E}$ to be as close to 1 as possible.

In a similar spirit, some designers also define a base transport factor $\gamma_{B}$ as the fraction of the minority carriers injected from the emitter into the base, $i_{E e}$, that flows into the collector, $-i_{C F}$ :

$$
\begin{equation*}
\gamma_{B} \equiv-\frac{i_{C F}}{i_{E e}} \tag{8.32a}
\end{equation*}
$$

Using Eq. (8.8) we find that, in terms of $\delta_{B}, \gamma_{B}$ is

$$
\begin{equation*}
\gamma_{B}=1-\delta_{B} \tag{8.32b}
\end{equation*}
$$

Again it is clear that this is a factor we want to design to be as close to 1 as possible.

When written in terms of $\gamma_{E}$ and $\gamma_{B}$, the forward alpha $\alpha_{F}$ takes on a particularly simple form:

$$
\begin{equation*}
\alpha_{F}=\gamma_{E} \gamma_{B} \tag{8.33a}
\end{equation*}
$$

whereas $\beta_{F}$ is a bit more complicated:

$$
\begin{equation*}
\beta_{F}=\frac{\gamma_{E} \gamma_{B}}{1-\gamma_{E} \gamma_{B}} \tag{8.33b}
\end{equation*}
$$

From both expressions, the desirability of keeping $\gamma_{E}$ and $\gamma_{B}$ as close as possible to 1 is clear.

## Example

Question. Consider a silicon npn transistor, similar in structure to the device pictured in Fig. 8.2, with the following dimensions and properties. The emitter, base, and collector dopings $-N_{D E}, N_{A B}$, and $N_{D C}$-are $5 \times 10^{17} \mathrm{~cm}^{-3}, 1 \times 10^{16} \mathrm{~cm}^{-3}$, and $1 \times 10^{15} \mathrm{~cm}^{-3}$, respectively. The effective widths of the emitter, base, and collector$w_{E}^{*}, w_{B}^{*}$, and $w_{C}^{*}$-are $1 \mu \mathrm{~m}, 0.25 \mu \mathrm{~m}$, and $5 \mu \mathrm{~m}$, respectively. The electron and hole diffusion coefficients are $40 \mathrm{~cm}^{2} / \mathrm{s}$ and $15 \mathrm{~cm}^{2} / \mathrm{s}$, respectively. The minority carrier lifetime in the base is $1 \mu \mathrm{~s}$. The device is at room temperature, and $n_{i}=$ $1 \times 10^{10} \mathrm{~cm}^{-3}$. What are the defects, $\delta_{E}, \delta_{B}$, and $\delta_{C}$; what are the emitter efficiency and base transport factor, $\gamma_{E}$ and $\gamma_{B}$; and what are the forward and reverse alphas, $\alpha_{F}$ and $\alpha_{R}$ ? Also, what are the forward and reverse betas, $\beta_{F}$ and $\beta_{R}$ ? Finally, what are the emitter and collector saturation current densities, $J_{E S}$ and $J_{C S}$ ?

Discussion. We calculate the defects first, using Eqs. (8.7), (8.11), and (8.20b), and find that $\delta_{E}$ is $2 \times 10^{-3}, \delta_{B}$ is $8 \times 10^{-6}$, and $\delta_{C}$ is 0.2 . We find that $\gamma_{E}$ is 0.998 and $\gamma_{B}$ is 0.999992 (or, for all practical purposes, 1 , because it is much closer to 1 than is $\gamma_{E}$ ). Notice that the base defect is very small; this is a very typical result in modern, narrow-base transistors.

Using the defects to calculate the forward and reverse alphas, we find that $\alpha_{F}$ is 0.998 and $\alpha_{R}$ is 0.83 . The corresponding forward and reverse betas, $\beta_{F}$ and $\beta_{R}$, are 500 and 5 , respectively. As we anticipated because of the device asymmetry, the reverse gain is much lower than the forward gain. Notice also that the forward beta is dominated by the emitter defect, consistent with the very small base defect.

Finally, we calculate the emitter and collector saturation current densities, $J_{E S}$ and $J_{C S}$, to be $1.25 \times 10^{-9} \mathrm{~A} / \mathrm{cm}^{2}$, and $1.5 \times 10^{-9} \mathrm{~A} / \mathrm{cm}^{2}$, respectively.

### 8.1.7 Beyond Ebers-Moll: Limitations of the Model

The model we have presented for the bipolar junction transistor is very simple. Therefore, although it does a remarkable job of describing the BJT and illuminates many of the basic issues in BJT design, it does neglect many effects. These effects tend to be important not so much in the normal forward active region of the device but rather in setting the limits on what the normal operating region of a given structure is. We will next look briefly at the following issues: (1) base width modulation, (2) punch-through, (3) base-collector junction breakdown, (4) space charge layer recombination, (5) high level injection, (6) emitter crowding, (7) series resistances, and (8) nonuniform doping profiles.
a) Base width modulation. In a transistor in which $N_{A B}$ is greater than $N_{D C}$, operating in the forward active region, the depletion region width on the base side of the base-collector junction varies very little with $v_{C B}$ (but it does vary some) and $w_{B}^{*}$ decreases with increasing $\left|v_{C B}\right|$. Consequently, $\delta_{B}$ and $\delta_{E}$ also both decrease and $\beta_{F}$ increases. This leads to a fanning out of the transistor output family of characteristics, as illustrated in Fig. 8.12. [The effect is severe in this


FIGURE 8.12
Output characteristics of a bipolar transistor with severe base width modulation, or Early effect. As indicated, the Early effect in a device is often characterized by extrapolating the curves back to a common voltage point on the voltage axis; this voltage $V_{A}$ is called the Early voltage of the device.
figure; devices can be made (by heavily doping the base, for example) in which base width modulation is barely observable in the characteristics.]
b) Punch-through. Punch-through is the extreme case of base width modulation where the base-collector junction space charge layer reaches through to the emitter and $w_{B}^{*}$ goes to zero. At this point the collector current increases uncontrollably and all transistor action is lost. This is in itself not a destructive process, but if the current is not limited by the circuit in which the transistor is being used, the device may be destroyed by excessive Joule $\left(i^{2} R\right)$ heating.
c) Base-collector junction breakdown. The base-collector junction will eventually break down as its reverse bias is increased further and further. Once this happens, all control over the collector current is again lost and the transistor is no longer useful.

Both punch-through and base-collector junction breakdown appear in the transistor characteristics as a sharp, essentially $i_{B}$-independent increase in $i_{C}$ at some critical $v_{B C}$ (or $v_{C E}$ ); the characteristic of a device displaying base-collector junction break-down is shown in Fig. 8.13. Neither process is in and of itself destructive, but any resulting excessive device heating can be.

In most devices junction breakdown will be the determining factor in setting the maximum voltage rating of a transistor. Thus, in designing a transistor to have a certain voltage rating, the doping of the collector is chosen to be just low enough that the junction breakdown voltage exceeds the desired rating. Making the doping level any lower needlessly increases the resistance of the collector region. Similarly, the thickness of the collector is made only large enough to accommodate the depletion region at the maximum reverse bias. Making it any thicker again adds needless resistance, whereas making it thinner will reduce the breakdown voltage.


FIGURE 8.13
Output characteristics of a bipolar junction transistor showing base-collector junction breakdown at large $v_{C E}$.
d) Space-charge layer recombination. At low forward biases, the emitter-base junction current may have an appreciable component of space-charge layer recombination current and the emitter defect will appear to be much greater than it is in the region where the current is limited by diffusion. Thus $\alpha_{F}$ and $\beta_{F}$ will be smaller at low current levels. If we plot $\beta_{F}$ (obtained by measuring $i_{C}$ and $i_{B}$ and calculating $i_{C} / i_{B}$ ) as a function of $i_{C}$, a typical variation might look like that in Fig. 8.14 (we will discuss the high-current decrease in $\beta_{F}$ in the next section).

Another type of plot that is often used to see this effect is called a Gummel plot. In a Gummel plot, the collector and base currents, $i_{C}$ and $i_{B}$, on a log scale are graphed versus the base-emitter voltage $v_{B E}$ on a linear scale. An example is shown in Fig. 8.15, where the dashed straight lines represent the ideal exponential behavior and the solid curve is the measured data. Since both $i_{C}$ and $i_{B}$ are plotted


FIGURE 8.14
Typical variation of $\beta_{F}$ with collector current level.


FIGURE 8.15
Gummel plot of the collector and base currents versus the base-emitter voltage on a log-linear scale. The effects of space-charge layer recombination at low current levels and of high-level injection and series resistance at high current levels are clearly seen as deviations from the ideal (dashed) curves.
on a log scale their ratio $\beta_{F}$ is proportional to the vertical distance between these two curves. The curves move closer together at high and low values of $i_{C}$ (and, equivalently, $v_{B E}$ ), showing the same $\beta_{F}$ decrease as in Fig. 8.14. The effects of space-charge layer recombination are evident at low $\nu_{B E}$, where the base current is higher than expected from the exponential model; whereas the deviations at higher values of $v_{B E}$ are due to effects that we will discuss in the next subsections.
e) High-level injection. At high forward biases, the emitter-base junction current again deviates from our ideal diffusion-limited behavior. Since the base is the more lightly doped side of this junction, high-level injection conditions are reached in the base and the hole current first. The hole current fails to increase as quickly with $v_{E B}$ as does the electron current, and again the emitter defect increases and $\beta_{F}$ decreases. This, coupled with the emitter crowding effect discussed in the next subsection, leads to the decrease in $\beta_{F}$ at high collector currents seen in Figs. 8.14 and 8.15. It also accounts for the bending over of the $i_{C}$ and $i_{B}$ curves at high $\nu_{B E}$ (see also Fig. 7.8).
f) Emitter crowding. Based on the above discussion, it might seem that to make a higher-current transistor we can simply make a device with a larger-area emitter-
base junction, but simply increasing the junction area does not work. Rather, it is the perimeter that must be increased. The problem lies in the fact that at high current levels there will be appreciable lateral voltage drop in the base region because of the resistance of the base layer. Thus the amount of forward bias on the emitter-base junction will decrease as one moves under the base region away from the outer edge. Since the amount of bias is small to begin with (i.e., 0.6 to 0.7 V in a silicon transistor) and the current is an exponential function of the bias, the inner portions of the emitter-base junction will not even be turned on if there is more than 0.1 or 0.2 V of lateral resistive voltage drop. Only the edges will be active. This effect is called emitter crowding. The emitter current is essentially crowded to the outside edges, the periphery, of the junction at high levels, so the junction perimeter rather than the total junction area determines the high-current performance. For this reason power transistors are designed with an emitter composed of many thin fingers, each sufficiently narrow that no part of the junction is more than a few microns from the thicker base contact region.
g) Series resistances. In the Ebers-Moll model, resistive voltage drops in the quasineutral regions are neglected. At high current levels, particularly, the resistance of the quasineutral region in the collector, as well as the sheet resistance of the base, must be taken into account. We have already discussed the design of the collector region to minimize the collector resistance and the role of the base resistance in limiting the transistor current. We will do nothing further with these resistances in our large-signal modeling of the BJT, but we will have more to say about them when we discuss incremental transistor models.
h) Nonuniform doping profiles. Uniformly doped emitter and base regions are rarely encountered in bipolar transistors, and the assumption of uniform $N_{E}$ and $N_{B}$ made during the development of the Ebers-Moll model does not really apply to many actual devices. Fortunately, it turns out to be relatively simple to account quite accurately for the nonuniform doping and "fix" the model. Where the products $N_{E} w_{E}^{*}$ and $N_{B} w_{B}^{*}$ appear in the Ebers-Moll expressions, we replace them, respectively, with

$$
\int_{-w_{E}}^{0^{-}} N_{E}(x) d x
$$

and

$$
\int_{0^{+}}^{w_{B}^{*}} N_{B}(x) d x
$$

These are simply the total doping concentrations per unit area in the emitter and base layers, respectively.

Nonuniformly doped regions and many of the other limitations in the EbersMoll model that we have pointed out are incorporated into the Gummel-Poon model for the bipolar transistor, which is the next step in sophistication past Ebers-Moll in large-signal modeling.

### 8.2 CIRCUIT MODELS FOR BIPOLAR JUNCTION TRANSISTORS

The Ebers-Moll equations describe the large-signal terminal characteristics of an ideal, quasi-one-dimensional bipolar junction transistor. We have seen that they can be conveniently represented by a circuit composed of ideal exponential diodes and dependent current sources (i.e., Fig. 8.7). Using this representation as a starting point we now want to develop models we can use in circuit analysis.

### 8.2.1 Large-Signal Models

The Ebers-Moll equations will be our starting point in developing large-signal circuit models for bipolar junction transistors. We will also go beyond that model and introduce the basic elements of the Gummel-Poon model as well. We will also add nonlinear charge stores to the model as a first step in analyzing the responses of BJTs to rapidly time-varying inputs.
a) Static models based on Ebers-Moll. The circuit representation of the EbersMoll equations in Fig. 8.7, which we repeat here in Fig. 8.16a, is our basic model for the terminal characteristics of a bipolar junction transistor. It is particularly

(a)

(b)

FIGURE 8.16
Circuit representations of the $n p n$ transistor Ebers-Moll model equations configured for use when (a) the terminal voltages are known; (b) the terminal currents are known.
useful when the terminal voltages, $v_{E B}$ and $v_{C B}$, are known. If, however, the terminal currents, $i_{E}$ and $i_{C}$, are known, then it is more convenient to use the equivalent circuit shown in Fig. 8.16b. In this figure the dependent sources depend on the terminal currents rather than the diode currents. A little algebra will show that the models in Figs. 8.16a and $b$ are equivalent if

$$
\begin{equation*}
I_{E O}=I_{E S}\left(1-\alpha_{F} \alpha_{R}\right) \tag{8.34a}
\end{equation*}
$$

and

$$
\begin{equation*}
I_{C O}=I_{C S}\left(1-\alpha_{F} \alpha_{R}\right) \tag{8.34b}
\end{equation*}
$$

For a pnp transistor we simply reverse the diodes in the circuit representations to obtain the models in Figs. 8.17a and $b$. Note that the definitions of $i_{F}$ and $i_{R}$ and the polarities of the dependent current sources are, by convention, also changed. The Ebers-Moll equations for a pnp transistor become

$$
\begin{gather*}
i_{E}=I_{E S}\left(e^{q \nu_{E B} / k T}-1\right)-\alpha_{R} I_{C S}\left(e^{q \nu_{C B} / k T}-1\right)  \tag{8.35a}\\
i_{C}=-\alpha_{F} I_{E S}\left(e^{q \nu_{E B} / k T}-1\right)+I_{C S}\left(e^{q \nu_{C B} / k T}-1\right) \tag{8.35b}
\end{gather*}
$$

## Example

Question. Consider a pnp transistor with the same emitter, base, and collector doping levels as the npn transistor in the preceding example. The two transistors are

(a)

(b)

FIGURE 8.17
Circuit representations of a pnp BJT: (a) when the terminal voltages are known; (b) when the terminal currents are known.
identical in all other relevant ways as well. What are the emitter, base, and collector defects, $\delta_{E}, \delta_{B}$, and $\delta_{C}$, in this device, and what are the forward and reverse alphas and betas?

Discussion. Our calculations proceed as before, except that the electron and hole diffusion coefficients switch roles, a change that reduces the gains and increases the defects. We now calculate that $\delta_{E}$ is $1.3 \times 10^{-2}, \delta_{B}$ is $2 \times 10^{-5}$, and $\delta_{C}$ is 6.7. Correspondingly, $\alpha_{F}$ is 0.987 and $\alpha_{R}$ is $0.13 ; \beta_{F}$ is now 76 and $\beta_{R}$ is 0.15 . The poorer characteristics of the pnp structure compared to the $n p n$ structure are one of the main reasons why $n p n$ is the preferred bipolar transistor type.

The full Ebers-Moll model is necessary if we are dealing with completely general terminal voltages, but we usually work in more restricted regions; in such cases it is often possible to simplify the model. For example, we are often interested in situations in which the base-collector junction is reverse-biased and the emitter-base junction is forward-biased. In this situation, the current $i_{R}$ will be essentially $-I_{C S}$ and will be negligible relative to $i_{F}$ and $\alpha_{F} i_{F}$. The Ebers-Moll model circuit can then be approximated as illustrated in Fig. 8.18a. We have, for a $p n p$,

$$
\begin{equation*}
i_{E} \approx I_{E S} e^{q \nu_{E B} / k T} \tag{8.36}
\end{equation*}
$$

and

$$
\begin{equation*}
i_{C} \approx-\alpha_{F} i_{E} \tag{8.37}
\end{equation*}
$$

It is also convenient to relate the collector current to the base current. We can write $i_{B}$ as

$$
\begin{equation*}
i_{B}=-i_{E}-i_{C} \tag{8.38a}
\end{equation*}
$$

which, using Eq. (8.37), becomes

$$
\begin{equation*}
i_{B}=-\left(1-\alpha_{F}\right) i_{E} \tag{8.38b}
\end{equation*}
$$

Substituting Eq. (8.36) into this yields

$$
\begin{equation*}
i_{B}=-\left(1-\alpha_{F}\right) I_{E S} e^{q v_{E B} / k T} \tag{8.38c}
\end{equation*}
$$

We write this as

$$
\begin{equation*}
i_{B}=-I_{B S} e^{q \nu_{E B} / k T} \tag{8.38d}
\end{equation*}
$$

where in the last equation we have defined $\left(1-\alpha_{F}\right) I_{E S}$ as $I_{B S}$. We can further write

$$
\begin{equation*}
i_{C}=\frac{\alpha_{F}}{\left(1-\alpha_{F}\right)} i_{B} \tag{8.39a}
\end{equation*}
$$

Recalling that $\beta_{F}=\alpha_{F} /\left(1-\alpha_{F}\right)$ [see Eq. (8.17b)], we see that this can be written as

$$
\begin{equation*}
i_{C}=\beta_{F} i_{B} \tag{8.39b}
\end{equation*}
$$

Circuit representations of Eqs. (8.38) and (8.39) are shown in Figs. $8.18 b$ and c. All of these representations are equivalent, and each is more useful than the others in certain situations.

$p n p$

$n p n$
(a)

$n p n$
(b)

$p n p$

$n p n$
(c)

FIGURE 8.18
Approximate large-signal models for bipolar junction transistors based on the Ebers-Moll model, valid when the base-collector junction is reverse-biased and $\left|I_{C S}\right|$ is negligible. The figures to the right correspond to $n p n$ transistors, those on the left to pnp transistors. The models in (a) are common-base models derived directly from the Ebers-Moll models by setting $I_{C S}$ equal to zero. The models in (b) are common-emitter models derived directly from those in (a) simply by writing $i_{C}$ as $\beta_{F} i_{B}$ [Eq. (8.39b)] rather than as $-\alpha_{F} i_{E}$ [Eq. (8.37)]. The models in (c) extend those in ( $b$ ) one step further by moving the diode from the emitter leg of the circuit to the base leg, which requires that we also change the saturation current of the diode from $I_{E S}$ to $I_{B S}$ [see the discussion following Eq. (8.38d)],

It is often unnecessary to use the full exponential diode model for largesignal analysis of bipolar transistor circuits. The $0.6-\mathrm{V}$ breakpoint model, Fig. $7.12 e$, is usually adequate. For example, using this model for the base-emitter diode in the npn model of Fig. 8.18c yields the transistor model illustrated in Fig. 8.19a. This npn model is very widely employed for large-signal bipolar transistor circuit analysis. The corresponding pnp model should be obvious.

Often in large-signal analysis it is important to determine the onset of cutoff and saturation. The model of Fig. $8.19 a$ is useful for addressing the issue of cutoff (i.e., the point at which the base-emitter diode turns off), but it gives us no information on saturation, which is the point at which the base-collector junction begins to coniduct. The solution to this shortcoming is to add a second breakpoint diode to the model between the base and collector terminals, as illustrated in Fig. 8.19b. In the forward active region this diode is open and does not enter the model. As the base-collector junction becomes forward biased, however, it eventually begins to conduct.

The question of just when the base-collector junction begins to conduct and a transistor enters saturation is an interesting one. Referring to Fig. 8.19b, note that the breakpoint voltage of the base-collector diode of a silicon transistor has been taken to be 0.4 V rather than 0.6 V . If you recall our discussion near the end of Sec. 7.4.1, there is no abrupt turn-on voltage in an exponential diode; rather, the choice is a matter of degree. In this case then, we want to say that we are in saturation and that the transistor has left its forward active region as soon as the diode starts to conduct a "little bit." We don't want to wait until it is forward-biased by 0.6 V and is really "on"; rather, we say that 0.4 V is sufficiently "on" to be of concern. Recall also that $I_{C S}$ is typically much larger than $I_{E S}$,


FIGURE 8.19
Large-signal npn transistor models incorporating breakpoint diode models: (a) the equivalent of the model in Fig. 8.18c; (b) the model modified to predict the onset of saturation. (The quiescent point notation is used for the base current in this figure to emphasize that these models are used primarily for bias point analysis. The numerical values given refer to silicon transistors.)
so the current through the base-collector diode biased to 0.4 V may very well be comparable to that through the emitter-base diode with 0.6 V bias.
b) Beyond Ebers-Moll, toward Gummel-Poon. We mentioned in the preceding discussion of limitations of the simple Ebers-Moll model that there is another model, called the Gummel-Poon model, in which effects such as nonuniform doping of the emitter, base, and collector regions, and space-charge layer recombination are taken into account. Although the development of this model is not beyond our ability, it is beyond our needs, so we will not do it. However, we can obtain the basic Gummel-Poon model from our Ebers-Moll model, which is worth the effort.

The basic Gummel-Poon model is shown in Fig. 8.20. It is developed using a formulation of the current flow problem that lets us treat nonuniformly doped regions, so it is more general than the approach used in the Ebers-Moll model. At the same time, however, the approaches are equivalent for transistors with uniformly doped emitters, bases, and collectors, and the basic Gummel-Poon for a uniformly doped transistor can easily be obtained from the Ebers-Moll model. The process is illustrated in Fig. 8.21 and is described in the following several paragraphs.

We first draw the Ebers-Moll model with the emitter down, as in Fig. 8.21a. Then we add two pairs of equal-magnitude, oppositely directed, dependent current


FIGURE 8.20
Basic Gummel-Poon model for the bipolar junction transistor. This model is also called the large-signal hybrid-pi model. It is commonly drawn with the emitter terminal down and the base terminal to the left, reffecting the most common connection of bipolar transistors in circuits.

(a)

(b)


E
(c)

(d)

FIGURE 8.21
Transformation of the Ebers-Moll model into the basic Gummel-Poon model: (a) the Ebers-Moll model drawn with the emitter down and the base terminal to the left; (b) parallel pairs of current sources added to the circuit; (c) parallel and series pairs of current sources combined to resimplify the circuit; ( $d$ ) redefinition of the diodes and dependent current source to complete the transformation.
sources in parallel with the original dependent sources, as shown in Fig. 8.21b. We next combine the left-most member of each of the two pairs of dependent current sources with the original generator. Having done this, we also recognize that since the right-most dependent sources are equal and connected in series, there must be no current flowing in the link connecting the midpoint of this pair of generators to the rest of the circuit. This link can therefore be broken without affecting the
performance of the circuit. Breaking this link does simplify the circuit, however, because the right-most two generators, being identical and connected in series, can now clearly be combined into one source. The resulting circuit is shown in Fig. 8.21c.

The next step is to note that the dependent current sources in parallel with the diodes are each dependent only on the current through its companion diode. Thus they can be combined with the diodes, and each combination can again be modeled as another ideal exponential diode. The saturation current of the diode between the base and emitter is $\left(1-\alpha_{F}\right) I_{E S}$; the saturation current of the diode between the base and collector is $\left(1-\alpha_{R}\right) I_{C S}$. This is illustrated in Fig. 8.21d.

When we combine the current sources and diodes to simplify the circuit, we have to realize that the other dependent current source (i.e., the one between the collector and emitter) depends on the currents through the original diodes. If those diodes disappear, we must recalculate the dependence of the current sources in terms of some current that we can still clearly identify or in terms of the terminal voltages. To do this and proceed, we next define two currents, $i_{F}^{\prime}$ and $i_{R}^{\prime}$, as shown in Fig. 8.21d. The current source between the collector and emitter will then clearly depend on both $i_{F}^{\prime}$ and $i_{R}^{\prime}$; it can be written as $a i_{F}^{\prime}+b i_{R}^{\prime}$. To see what $a$ and $b$ are, refer to Fig. 8.21c, from which it is clear that $a i_{F}^{\prime}$ must be $\alpha_{F} i_{F}$, and $b i_{R}^{\prime}$ must be $-\alpha_{R} i_{R}$. Writing $i_{F}^{\prime}, i_{F}, i_{R}^{\prime}$, and $i_{R}$ in terms of $v_{B E}, v_{B C}$, and the diode parameters, we have

$$
\begin{equation*}
a\left(1-\alpha_{F}\right) I_{E S}\left(e^{q \nu_{B E} / k T}-1\right)=\alpha_{F} I_{E S}\left(e^{q \nu_{B E} / k T}-1\right) \tag{8.40}
\end{equation*}
$$

and

$$
\begin{equation*}
b\left(1-\alpha_{R}\right) I_{C S}\left(e^{q v_{B C} / k T}-1\right)=-\alpha_{R} I_{C S}\left(e^{q \nu_{B C} / k T}-1\right) \tag{8.41}
\end{equation*}
$$

from which we see immediately that $a$ is $\alpha_{F} /\left(1-\alpha_{F}\right)$, which we see from Eq. 8.17 b is just $\beta_{F}$; and $b$ is $-\alpha_{R} /\left(1-\alpha_{R}\right)$, which is just $-\beta_{R}$. This result is also shown in Fig. 8.21d.

The final step that we take is to define a new saturation current $I_{S}$, given by

$$
\begin{equation*}
I_{S} \equiv \alpha_{F} I_{E S}=\alpha_{R} I_{C S} \tag{8.42}
\end{equation*}
$$

and to notice that in terms of $I_{S}$ the saturation currents of the new diodes between the base and emitter and the base and collector are $I_{S} / \beta_{F}$ and $I_{S} / \beta_{R}$, respectively. We can then write the dependent current source, $\beta_{F} i_{F}^{\prime}-\beta_{R} i_{R}^{\prime}$, as follows:

$$
\begin{equation*}
\beta_{F} i_{F}^{\prime}-\beta_{R} i_{R}^{\prime}=I_{S}\left(e^{q \nu_{B E} / k T}-1\right)-I_{S}\left(e^{q \nu_{B C} / k T}-1\right) \tag{8.43a}
\end{equation*}
$$

which in turn simplifies to

$$
\begin{equation*}
\beta_{F} i_{F}^{\prime}-\beta_{R} i_{R}^{\prime}=I_{S}\left(e^{q \nu_{B E} / k T}-e^{q \nu_{B C} / k T}\right) \tag{8.43b}
\end{equation*}
$$

This definition of $I_{S}$ and these expressions for the diode saturation currents and dependent current source give us the basic Gummel-Poon model in Fig. 8.20.

We can now use our earlier expressions for $I_{E S}, \alpha_{F}, \delta_{E}$, and $\delta_{B}$ in terms of the device dimensions and other parameters, that is, Eqs. (8.12), (8.14), (8.7), and (8.11), respectively, to obtain a similar equation for $I_{S}$. We can write

$$
\begin{equation*}
I_{S}=q A n_{i}^{2} \frac{D_{e}}{N_{A B} w_{B}^{*}}\left(1-\delta_{B}\right)=q A n_{i}^{2} \frac{D_{e}}{N_{A B} w_{B}^{*}}\left[1-\frac{\left(w_{B}^{*}\right)^{2}}{2 L_{e B}^{2}}\right] \tag{8.44}
\end{equation*}
$$

Before continuing, look at Eq. (8.43a) and consider whether it makes sense in light of what you know about the physics of a bipolar transistor: the excess electron concentration at the edge of the base nearest the emitter is proportional to ( $e^{q \nu_{B E} / k T}-1$ ), and that at the collector edge is proportional to ( $e^{q v_{B C} / k T}-1$ ). The minority carrier diffusion current across the base from emitter to collector should therefore be proportional to their difference, which is just what Eq. (8.43a) says. A little thought will further show you that the proportionality factor should be $q A n_{i}^{2} D_{e} / N_{A B} w_{B}^{*}$ multiplied by ( $1-\delta_{B}$ ), which is the fraction of the minority carriers injected at the emitter that successfully transit the base. This, of course, is just what Eq. (8.44) says.

Efforts to add "nonideal" effects to models for the terminal characteristics of bipolar junction transistors usually begin with the basic Gummel-Poon model. We mentioned earlier that the effects of nonuniform doping in the various regions of the device can be included by replacing the doping-concentration/layer-width product that appears several places in the Ebers-Moll model with the integral of the doping profile over the layer. An obvious example is in the expression for $I_{S}$ in Eq. (8.44). The effects of space-charge layer recombination are easily included by adding two $n=2$ exponential diodes between the base and emitter and the base and collector, respectively, just as we did with the diode in Sec. 7.4.1b.

High-level injection effects can be added to the model as we did with the diode in Sec. 7.4.1b, but more commonly we handle them by expanding the model for $\beta_{F}$ to include a dependence on the collector current because the main impact of high-level injection is on $\beta_{F}$ anyway. In an ad hoc manner we say that $\beta_{F}$ varies as

$$
\begin{equation*}
\beta_{F}=\frac{\beta_{F 0}}{1+I_{C} / I_{K F}} \tag{8.45}
\end{equation*}
$$

where $\beta_{F 0}$ is the zero- (i.e. low-) current forward beta and $I_{K F}$ is the current level at which $\beta_{F}$ has fallen to half its low-current value. A similar model is used for the reverse beta $\beta_{R}$.

Another effect that is often included in the Ebers-Moll model for a bipolar transistor is series resistance in the device leads. Looking back at the cross section of a typical BJT in Fig. 8.1, it is not surprising that there may at times be significant resistances in series with at least the base and collector leads. The possibility of significant resistance in series with the emitter is less obvious; in fact, the emitter series resistance tends to be small, but it is not zero, and in certain instances even a small emitter resistance can have significant consequences. To model these resistances, suitable-value resistors can easily be added to the model in series with the emitter, base, and collector leads. A model including elements to account for all of these effects is shown in Fig. 8.22.


FIGURE 8.22
BJT model containing elements to account for space-charge layer recombination and series lead resistances.

Finally, base width modulation, or the Early effect*, is typically taken into account through the variation of $I_{S}$ with $w_{B}^{*}$ [see Eq. (8.44)]. The dependence of $w_{B}^{*}$ on $v_{B C}$ and $v_{B E}$ is, as you can appreciate, messy mathematically, but experience has shown that a useful fit to device characteristics can be obtained by the following relatively simple expression:

$$
\begin{equation*}
w_{B}^{*}\left(v_{B E}, v_{B C}\right)=\frac{w_{B}^{*}(0,0)}{1+\left(v_{B C} / V_{A}\right)+\left(v_{B E} / V_{L}\right)} \tag{8.46}
\end{equation*}
$$

where $V_{A}$ is called the Early voltage and $V_{L}$ is called either the reverse Early voltage, or, believe it or not, the Late voltage. ${ }^{\dagger} V_{L}$ accounts for the Early effect in the reverse mode of operation. Equation (8.46) is used where $w_{B}^{*}$ appears in the first factor in Eq. (8.44) for $I_{S}$, but where $\left(w_{B}^{*}\right)^{2}$ appears in $\delta_{B}$ its variation with voltage is neglected.
c) Dynamic models with charge stores. To extend our bipolar transistor models to dynamic situations it may be necessary to account for the charge stored in the

[^4]device, just as we had to do in Sec. 7.4.1c for the $p-n$ diode. In the BJT, the most important charge stores are those associated with the $p$ - $n$ junctions. They can be modeled by adding nonlinear capacitors in parallel with the diodes representing the two junctions in the Ebers-Moll and/or the Gummel-Poon model. For purposes of illustration, this is done in Fig. 8.23 for the BJT model from Fig. 8.22.

### 8.2.2 Static Small-Signal Linear Models

Our primary motivation for developing small-signal linear models for bipolar junction transistors is that if we can find linear relationships between the terminal variables, then there are many possible applications of these devices in linear circuits, such as audio amplifiers. It is also true, moreover, that nonlinear equations are difficult to treat analytically and that we have numerous linear circuit analysis techniques at our disposal, which we can use once we have linear models. This is also an important consideration.
a) Common-emitter models. We proceed in a rather general way by performing a linear expansion of the transistor terminal characteristics about a quiescent operating point. The most useful model for us will be one in which the emitter terminal is common to both the input and the output circuit, so we select our


FIGURE 8.23
BJT model from Fig. 8.22 modified by adding two nonlinear capacitors to account for the nonlinear charge stores associated with the emitter-base and base-collector $p-n$ junctions.
voltages as $v_{B E}$ and $v_{C E}$ and our currents as $i_{B}\left(v_{B E}, v_{C E}\right)$ and $i_{C}\left(v_{B E}, v_{C E}\right)$. We will discuss other choices of variables later.

Assume that our quiescent operating point $Q$ is $\left(V_{B E}, V_{C E}\right)$ and thus our expansions of $i_{B}$ and $i_{C}$ are

$$
\begin{align*}
i_{B}\left(v_{B E}, v_{C E}\right) & =i_{B}\left(V_{B E}, V_{C E}\right)+\left.\frac{\partial i_{B}}{\partial v_{B E}}\right|_{Q}\left(v_{B E}-V_{B E}\right) \\
& +\left.\frac{\partial i_{B}}{\partial v_{C E}}\right|_{Q}\left(v_{C E}-V_{C E}\right)+\text { Higher-order terms } \tag{8.47a}
\end{align*}
$$

and

$$
\begin{align*}
i_{C}\left(v_{B E}, v_{C E}\right) & =i_{C}\left(V_{B E}, V_{C E}\right)+\left.\frac{\partial i_{C}}{\partial v_{B E}}\right|_{Q}\left(v_{B E}-V_{B E}\right) \\
& +\left.\frac{\partial i_{C}}{\partial v_{C E}}\right|_{Q}\left(v_{C E}-V_{C E}\right)+\text { Higher-order terms } \tag{8.47b}
\end{align*}
$$

Recognizing that $i_{B}\left(V_{B E}, V_{C E}\right)$ is $I_{B} ; i_{C}\left(V_{B E}, V_{C E}\right)$ is $I_{C} ;\left(v_{B E}-V_{B E}\right)$ is $v_{b e}$; ( $v_{C E}-V_{C E}$ ) is $v_{c e} ;\left(i_{B}-I_{B}\right)$ is $i_{b}$; and $\left(i_{C}-I_{C}\right)$ is $i_{c}$; and assuming that $v_{b e}$ and $v_{c e}$ are small enough that we can ignore the higher-order terms, we have

$$
\begin{equation*}
i_{b}=\left.\frac{\partial i_{B}}{\partial v_{B E}}\right|_{Q} v_{b e}+\left.\frac{\partial i_{B}}{\partial v_{C E}}\right|_{Q} v_{c e} \tag{8.48a}
\end{equation*}
$$

and

$$
\begin{equation*}
i_{c}=\left.\frac{\partial i_{C}}{\partial v_{B E}}\right|_{Q} v_{b e}+\left.\frac{\partial i_{C}}{\partial v_{C E}}\right|_{Q} v_{c e} \tag{8.48b}
\end{equation*}
$$

The partial derivatives have the units of conductance and are given the following names:

$$
\begin{align*}
& \left.\frac{\partial i_{B}}{\partial v_{B E}}\right|_{Q} \equiv g_{\pi}, \text { input conductance }  \tag{8.49}\\
& \left.\frac{\partial i_{B}}{\partial v_{C E}}\right|_{Q} \equiv g_{r}, \text { reverse transconductance }  \tag{8.50}\\
& \left.\frac{\partial i_{C}}{\partial v_{B E}}\right|_{Q} \equiv g_{m}, \text { forward transconductance }  \tag{8.51}\\
& \left.\frac{\partial i_{C}}{\partial v_{C E}}\right|_{Q} \equiv g_{0}, \text { output conductance } \tag{8.52}
\end{align*}
$$

The use of $g_{\pi}$ and $g_{m}$ for the input conductance and forward transconductance, respectively, rather than $g_{i}$ and $g_{f}$, for example, is a matter of convention that we will respect.

Thus far our small-signal modeling has been, except for our choice of a common-emitter configuration, purely a mathematical exercise. The specific device physics enters only when we evaluate the various conductances and transconductances using our large signal model. We assume that the quiescent operating
point $Q$ is in the forward active region of the transistor characteristics. In that case, the large-signal model reduces essentially to that of Fig. 8.18b. We see immediately that there is no dependence of the terminal currents on $v_{C E}$, so $g_{r}$ and $g_{0}$ are both identically zero.

Turning next to $g_{m}$, we can use Eqs. (8.38) and (8.39) to obtain

$$
\begin{equation*}
g_{m}=\frac{q}{k T} \beta_{F} I_{B S} e^{q V_{B E} / k T} \tag{8.53a}
\end{equation*}
$$

which can be conveniently written as

$$
\begin{equation*}
g_{m}=q \frac{\left|I_{\mathcal{C}}\right|}{k T} \tag{8.53b}
\end{equation*}
$$

Similarly we find that $g_{\pi}$ is given by

$$
\begin{equation*}
g_{\pi}=\frac{q}{k T} I_{B S} e^{q V_{B E} / k T} \tag{8.54a}
\end{equation*}
$$

We could write this as $q I_{B} / k T$, but it turns out that a more practical and more general way of writing this is in terms of $g_{m}$. Comparing this last equation to the first expression we obtained for $g_{m}$, we find that $g_{\pi}$ and $g_{m}$ are related as

$$
\begin{equation*}
g_{\pi}=\frac{g_{m}}{\beta_{F}} \tag{8.54b}
\end{equation*}
$$

We will use Eqs. (8.53) and (8.54b) to evaluate $g_{m}$ and $g_{\pi}$, respectively, in this text. It turns out that in situations where $\beta$ varies with the collector current, Eq. (8.54b) is a valid expression for $g_{\pi}$ as long as $\beta_{F}$ is replaced with $\beta_{f} \equiv$ $\partial i_{C} /\left.\partial i_{B}\right|_{Q}$. This issue is discussed further in App. F.

A linear circuit representing the small-signal linear model we have developed for the bipolar junction transistor is shown in Fig. 8.24a. This model is valid for both $n p n$ and $p n p$ transistors. You should take the time to convince yourself of this fact.

## Example

Question. Consider an npn bipolar transistor with a forward beta $\beta_{F}$ of 150 , and an $I_{C}$ of 1 mA . What are $g_{m}$ and $g_{\pi}$ for this device at this bias point? Assume room-temperature operation.

Discussion. Using Eqs. (8.53) and (8.54b), we find that the transconductance $g_{m}$ is 40 mS and that the input conductance $g_{\pi}$ is 0.267 mS . We often think in terms of resistance when we deal with the input of a device; inverting $g_{\pi}$, we see that the corresponding input resistance $r_{\pi}$ is $3.75 \mathrm{k} \Omega$. Notice that if $\beta_{F}$ were larger, $r_{\pi}$ would be larger ( $g_{\pi}$ smaller); and if $\beta_{F}$ were smaller, $r_{\pi}$ would be smaller ( $g_{\pi}$ larger). The value of $g_{m}$ does not change with $\beta_{F}$, assuming that $I_{C Q}$ remains unchanged.

We can modify our model slightly by changing the dependent current source from one that depends on $v_{b e}$, the voltage across $r_{\pi}$, to one that depends on $i_{b}$, the current through $r_{\pi}$. Because $i_{b}$ is $g_{\pi} v_{b e}$ and $g_{\pi}$ is $g_{m} / \beta$, the magnitude of the dependent current source, $g_{m} v_{b e}$, is also $\beta i_{b}$; the model can thus be redrawn


FIGURE 8.24
Static small-signal linear equivalent circuits for bipolar transistors in a common-emitter connection: (a) $g_{m}$ (transconductance) model; (b) $\beta_{f}$ (current gain) model; (c) $\beta$-model with zero base resistance.
equivalently as shown in Fig. 8.24b. This is a particularly useful configuration if $g_{\pi}$ is large, that is, if $r_{\pi}$ ( $\equiv 1 / g_{\pi}$ ) is small, which is frequently the case because a rough first approximation to the operation of a circuit can often be obtained by setting $r_{\pi}=0$. This model is drawn in Fig. 8.24c.
b) Common-base model. Sometimes a bipolar transistor is connected in a circuit with its base terminal common to the input and output. To model this so-called common-base connection, it is convenient to choose $v_{e b}$ and $v_{c b}$ as the independent variables and $i_{c}$ and $i_{e}$ as the dependent variables. We could proceed
exactly as we did for the common-emitter model, taking the two currents to be dependent on the two voltages, but for a little variety let us begin by writing $i_{e}\left(v_{e b}, v_{c b}\right)$ and $i_{c}\left(i_{e}, v_{c b}\right)$. We choose to make $i_{c}$ dependent on $i_{e}$, rather than on $v_{e b}$, because we expect a linear relationship between $i_{c}$ and $i_{e}$ based on the physics of the device. Because $i_{e}$ is a function of $v_{e b}$ and $v_{c b}, i_{c}$ can, of course, also be written as a function of $v_{e b}$ and $v_{c b}$ simply by inserting $i_{e}\left(v_{e b}, v_{c b}\right)$ into $i_{c}\left(i_{e}, v_{c b}\right)$.

Stating these observations another way, we have a certain mathematical flexibility in how we select our variables; physically, certain choices make more sense than others. You might ask why, when deriving the small-signal common emitter circuit, we did not use our knowledge of the device physics to initially write $i_{c}$ as dependent on $i_{b}$ and $v_{c e}$, rather than $v_{b e}$ and $v_{c e}$, and get the model of Fig. $8.24 b$ directly. Based strictly on static modeling this is a valid criticism. We will see in the next section when we discuss dynamic models, however, that our original choice that led to the model of Fig. $8.24 a$ is superior in some situations. We will also see when we discuss other types of transistors in later chapters that having the dependent current source at the output depend on the input voltage rather than on input current is more generic to the class of three terminal transistor-like devices.

Returning to the problem of obtaining a common-base model, we write

$$
\begin{equation*}
i_{e}=g_{e} v_{e b}+g_{r b} v_{c b} \tag{8.55}
\end{equation*}
$$

and

$$
\begin{equation*}
i_{c}=\alpha_{f} i_{e}+g_{o b} v_{c b} \tag{8.56}
\end{equation*}
$$

where we have

$$
\begin{align*}
g_{e} & \left.\equiv \frac{\partial i_{E}}{\partial v_{E B}}\right|_{Q}  \tag{8.57}\\
g_{r b} & \left.\equiv \frac{\partial i_{E}}{\partial v_{C B}}\right|_{Q}  \tag{8.58}\\
\alpha_{f} & \left.\equiv \frac{\partial i_{C}}{\partial i_{E}}\right|_{Q}  \tag{8.59}\\
g_{o b} & \left.\equiv \frac{\partial i_{C}}{\partial v_{C B}}\right|_{Q} \tag{8.60}
\end{align*}
$$

The subscript $b$ has been added to distinguish some of these quantities from the common-emitter parameters. Referring to our large-signal common-base model, Fig. $8.18 a$, we see that $g_{r b}$ and $g_{o b}$ must be zero and that $\alpha_{f}=\alpha_{F}$. The small-signal emitter resistance $g_{e}$ based on this same Ebers-Moll-based model is $q\left|I_{E}\right| / k T$. A more general expression, useful even when $\beta$ varies with $I_{E}$, can be obtained by manipulating the common-emitter models in Fig. 8.24. Doing so, we find that we can write both $\alpha_{f}$ and $g_{e}$ in terms of $g_{m}$ and $\beta_{f}$ as

$$
\begin{equation*}
\alpha_{f}=\frac{\beta_{f}}{\left(\beta_{f}+1\right)} \tag{8.61}
\end{equation*}
$$

and

$$
\begin{equation*}
g_{e}=\frac{g_{m}}{\alpha_{f}} \tag{8.62}
\end{equation*}
$$

We will use these expressions to calculate $\alpha_{f}$ and $g_{e}$. This common-base smallsignal model is illustrated in Fig. 8.25a.

If we were to use $i_{C}\left(v_{E B}, v_{C B}\right)$ rather than $i_{C}\left(i_{E}, v_{C B}\right)$, we would obtain the model of Fig. $8.25 b$, where $g_{m}$ is the same as for the common-emitter model.
c) Parasitic elements. The small-signal models we have developed are satisfactory in most low-frequency applications, but in certain situations it is necessary to include small effects that we have thus far neglected. There are two such "parasitic" elements we will consider: the output conductance $g_{o}$ and the base series resistance $r_{x}$.

In the Ebers-Moll model, the output conductance $g_{o}$ is zero, but in Sec. 8.1 .7 we saw that the Early effect, or base-width modulation, leads to a finite slope in the output characteristics. That is, $\partial i_{C} / \partial v_{C E}$ (i.e., $g_{0}$ ) is not identically zero. In such cases the Early voltage is an important device parameter to know because it enables us to calculate the incremental output conductance $g_{0}$ at any bias point in the forward active region. This is illustrated in Fig. 8.26. Assuming that $V_{A}$ is much greater than $V_{C E}$, we can approximate the slope of the characteristics (i.e., $g_{0}$ ) for a given quiescent output current $I_{C}$ as

$$
\begin{equation*}
g_{0} \cong \frac{\left|I_{C}\right|}{V_{A}} \tag{8.63}
\end{equation*}
$$



FIGURE 8.25
Common-base static small-signal linear equivalent circuits for a bipolar transistor: (a) $\alpha_{f}$ model; (b) $g_{m}$ model.


FIGURE 8.26
Output characteristics of an npn BJT illustrating the relationship between the Early voltage $V_{A}$, the quiescent collector current $I_{C}$, and the incremental output conductance $g_{o}$.

In a well-designed transistor, $g_{o}$ will be very small and can usually be approximated as zero. However, in situations where the performance depends on $g_{o}$ being zero, the fact that it is small but not exactly zero must be taken into account. Conceptually, it is often easier to think in terms of $1 / g_{o}$, which we define as the output resistance $r_{o}$. Typical values of $r_{o}$ are $10^{5}$ to $10^{6} \Omega$. When the circuit in which the transistor is found has resistances of $10^{4} \Omega$ or less in parallel with $r_{o}$, then $r_{o}$ can be neglected. If, however, resistances of comparable or larger magnitude than $r_{o}$ are in parallel with it, then $r_{o}$ must be included.

We also assumed in the Ebers-Moll model that the base current flowed in from the base contact unimpeded. Referring back to Fig. 8.1, however, we see that this contact is often far off to the side of the device. Furthermore, the base itself is quite thin and only moderately doped. Consequently there is some resistance to lateral current flow in the base and sometimes this resistance, which we will call the parasitic base resistance $r_{x}$, becomes important. Typical $r_{x}$ values are 25 to $50 \Omega$. The issue now is what other resistances are in series with $r_{x}$. In the common-emitter configuration, this other resistance is $r_{\pi}$. Usually, this resistance is on the order of $10^{3} \Omega$ and $r_{x}$ is negligibly smaller. In the common-base configuration, however, $r_{x}$ appears in series with $r_{e}\left(\approx 1 / g_{e}\right)$, which is considerably smaller (by a factor of roughly $\beta_{f}$ ) than $r_{\pi}$. In commonbase applications, then, $r_{x}$ may be a significant factor.

The low-frequency common-emitter small-signal equivalent circuit including $g_{0}$ and $r_{x}$ is shown in Fig. 8.27.

### 8.2.3 Dynamic Small-Signal Transistor Models

Following the same logic we employed with $p-n$ diodes, we will extend our static small-signal transistor models to high-frequency time-varying signals by adding the appropriate junction capacitances. There are two $p-n$ junctions in a bipolar transistor, the emitter-base junction and the base-collector junction.


FIGURE 8.27
Common-emitter small-signal equivalent circuit including the parasitic base resistance $r_{x}$ and the output conductance go.

In the forward active region the base-collector junction is reverse-biased, so there is negligible diffusion capacitance associated with this junction. The basecollector capacitance is thus exclusively depletion capacitance. By convention, we label this capacitor $C_{\mu}$.

The emitter-base junction is forward-biased, and the emitter-base junction voltage determines the amount of excess carrier injection into the base, so at this junction there is both diffusion and depletion capacitance. The sum of these two capacitances forms the emitter-base capacitance, which we label $C_{\pi}$.
$C_{\pi}$ and $C_{\mu}$ depend on the quiescent operating just as $g_{\pi}$ and $g_{m}$ do. The depletion capacitance contributions to them depend on the relevant junction voltage. The diffusion capacitance component of $C_{\pi}$ is most conveniently written in terms of the quiescent collector current $I_{C}$. Referring to Eq. (7.44'), we find that it can be written as

$$
\begin{equation*}
C_{e b, d f}=\frac{w_{B}^{* 2}}{2 D_{\min , B}} \frac{q}{k T}\left|I_{c}\right| \tag{8.64}
\end{equation*}
$$

where we assume that $\beta_{f}$ is large, so $I_{C} \approx I_{E}$ and there is negligible excess minority carrier injection into the emitter. Defining $\left(w_{B}^{*}\right)^{2} / 2 D_{\min , B}$ as the base transit time $\tau_{b}$ and recognizing $q\left|I_{C}\right| / k T$ as $g_{m}$, we can write this contribution to $C_{\pi}$ as

$$
\begin{equation*}
C_{e b, d f}=g_{m} \tau_{b} \tag{8.65}
\end{equation*}
$$

Notice that the diffusion capacitance contribution to $C_{\pi}$ increases with increasing $I_{C}$, which in turn increases exponentially with $V_{B E}$, whereas the depletion capacitance increases only slightly. Furthermore the diffusion capacitance does not depend on the diode area, whereas the depletion capacitance is directly proportional to this area. At high current levels, then, $C_{\pi}$ will be dominated by $C_{e b, d f}$ and it will dominate sooner in smaller devices. As we shall see in Chap. 14, it is advantageous for this reason to operate transistors at high current densities when high-speed operation is important.

Adding $C_{\mu}$ and $C_{\pi}$ to the common-emitter model, we obtain the circuit shown in Fig. 8.28a. This particular model is known as the hybrid- $\pi$ model. The capacitor $C_{\mu}$ is in a critical position, as we shall see in Chap. 14. It forms a bridge between the input and output that couples, or feeds back, some of the output signal to the input. Such feedback can have good as well as bad effects, but in this case it primarily tends to be an undesirable coupling. Notice, also, that it now becomes clear why we use a current source in the collector that depends on the voltage across $r_{\pi}$ rather than on the base current. The base current now includes current that flows into the two capacitors, $C_{\pi}$ and $C_{\mu}$, but it is only the current through $r_{\pi}$ that appears at the collector. It is much more convenient in practice, as we shall see, to keep track of $v_{\pi}$, the voltage across $r_{\pi}$, than it is to calculate the current through it.

In the common-base configuration, adding $C_{\mu}$ and $C_{\pi}$ yields the circuit in Fig. 8.28b. Notice that in this case there is no feedback between output and input. As with the common-emitter model, because the emitter current now includes current into $C_{\pi}$, it is most convenient to use the version of the model in which the dependent current source is a function of the voltage across $r_{e}$ rather than the current through it.

Finally, we should remind ourselves that we are still using a quasistatic model for the bipolar transistor, to which we have added junction capacitances in a rather ad hoc fashion. Strictly speaking, we still need to justify our assumption


FIGURE 8.28
High-frequency small-signal transistor models: (a) the common-emitter, or hybrid- $\pi$, model; (b) the common-base model.
that this is a valid approach (i.e., that the quasistatic description of the intrinsic bipolar transistor physics is still valid). We will return to this issue in Chap. 14 and demonstrate that our modeling is indeed justifiable after we first discuss circuit analysis at low frequencies and look at high-frequency limits to circuit performance.

### 8.3 PHOTOTRANSISTORS

In Chap. 7 we saw that interesting and useful things happen when we shine light on a $p-n$ diode. Interesting and useful things also happen when we illuminate a bipolar transistor. Bipolar transistors designed to respond to light are called phototransistors. We will discuss how they function and how they are constructed in this section.

To model the effect of illumination on a biased bipolar transistor, we will again use superposition. We already have a model, the Ebers-Moll model, for a bipolar transistor excited by externally applied voltages, so we will next develop a model for a bipolar transistor excited by light. The model we seek for a transistor disturbed from equilibrium by both applied voltages and light can be obtained by combining these two models.

Consider the one-dimensional $n p n$ transistor shown in Fig. 8.29a. Assume that the transistor's terminals are short-circuited so that the junction voltages, $v_{E B}$ and $v_{C B}$, are zero. Assume further that the transistor is illuminated by light that generates $M$ hole-electron pairs per $\mathrm{cm}^{2} \cdot \mathrm{~s}$ uniformly across the plane at $x=x_{l}$. If $x_{l}$ is in the base region between $0^{+}$and $w_{B}^{-}$, then the excess minority carrier concentration profile is like that shown in Fig. $8.29 b$ and the minority carrier current densities are as illustrated in Fig. 8.29c. If the cross-sectional area of the device is $A$, then the emitter current is $A q M f$ and the collector current is $A q M g$, where $f$ is between 0 and 1 and is given by $\left(w_{B}^{-}-x_{l}\right) /\left(w_{B}^{-}-0^{+}\right)$and where $g$ is ( $1-f$ ).

You should be able to convince yourself that if $x_{l}$ falls within the emitterbase junction depletion region (i.e., if $0^{-} \leq x_{l} \leq x^{+}$), then $f$ is 1 and $g$ is 0 ; and that if $x_{l}$ falls within the base-collector junction depletion region (i.e., $w_{B}^{-} \leq x_{l} \leq w_{B}^{+}$), then $f$ is 0 and $g$ is 1 . Furthermore, if the illumination falls in the emitter region (i.e., if $-w_{E} \leq x_{l} \leq 0^{-}$), then $g$ is equal to 0 and $f$ is $\left(-w_{E}-x_{l}\right) /\left(-w_{E}-0^{-}\right)$; whereas if the light falls in the collector [i.e., if $w_{B+} \leq$ $\left.x_{l} \leq\left(w_{B}+w_{C}\right)\right]$, then $f$ is 0 and $g$ is $\left(w_{C}+w_{B}-x_{l}\right) /\left(w_{C}+w_{B}-w_{B}^{+}\right)$.

To summarize, with a spatial impulse of illumination generating $q M$ pairs/ $\mathrm{cm}^{2} \cdot \mathrm{~s}$ uniformly across the plane at $x_{l}$, the short-circuit emitter and collector currents are, respectively,

$$
\begin{equation*}
i_{E}=A q M f \tag{8.66}
\end{equation*}
$$

and

$$
\begin{equation*}
i_{C}=A q M g \tag{8.67}
\end{equation*}
$$



FIGURE 8.29
(a) Short-circuited one-dimensional $n p n$ bipolar transistor illuminated with light generating $M$ hole-electron pairs $/ \mathrm{cm}^{2} \cdot \mathrm{~s}$ uniformly across the plane at $x=x_{l} ;(b)$ excess minority carrier distribution assuming $x_{l}$ is in the base region; (c) the corresponding minority carrier current distribution.
where the factors $f$ and $g$ take on the following values when $x_{l}$ is in each of five regions:

$$
\begin{array}{ll}
f=\frac{\left(-w_{E}-x_{l}\right)}{\left(-w_{E}-0^{-}\right)}, \quad g=0 & \text { for }-w_{E} \leq x_{l} \leq 0^{-} \\
f=1, \quad g=0 & \text { for } 0^{-} \leq x_{l} \leq 0^{+} \\
f=\frac{\left(w_{B}^{-}-x_{l}\right)}{\left(w_{B}^{-}-0^{+}\right)}, \quad g=1-f & \text { for } 0^{+} \leq x_{l} \leq w_{B}^{-} \\
f=0, \quad g=1 & \text { for } w_{B}^{-} \leq x_{l} \leq w_{B}^{+} \\
f=0, \quad g=\frac{\left(w_{C}+w_{B}-x_{l}\right)}{\left(w_{C}+w_{B}-w_{B}^{+}\right)} & \text {for } w_{B}^{+} \leq x_{l} \leq\left(w_{B}^{+}+w_{C}\right) \tag{8.68e}
\end{array}
$$

An equivalent circuit for these characteristics is shown in Fig. 8.30a. Combining the circuit of Fig. 8.30a with the Ebers-Moll model (Fig. 8.7) results in the complete large-signal phototransistor model shown in Fig. 8.30b.


FIGURE 8.30
(a) Large-signal equivalent circuit for the terminal characteristics of an illuminated short-circuited $n p n$ transistor; (b) the circuit in (a) combined with the Ebers-Moll model to give a large-signal equivalent for an npn bipolar phototransistor.

To see how the phototransistor differs from a photodiode, consider an npn phototransistor biased into its forward active region with $v_{C E}$ very positive (i.e., much greater than $k T / q$ ) and with the base terminal open-circuited (i.e., $i_{B}=0$ ). The base-collector junction is clearly reverse-biased, and $i_{R}$ is $I_{C S}$. We find after a little algebra that

$$
\begin{equation*}
i_{C}=-i_{E}=\left[\beta_{F}(f+g)+g\right] q M A+\frac{\left(1-\alpha_{F} \alpha_{R}\right)}{\left(1-\alpha_{F}\right)} I_{C S} \tag{8.69a}
\end{equation*}
$$

In a well-designed device, $I_{C S}$ will be much smaller than $q M A$ and $\beta_{F}$ will be much greater than 1 , so we can approximate this result as

$$
\begin{equation*}
i_{C}=-i_{E} \approx \beta_{F} q M A(f+g) \tag{8.69b}
\end{equation*}
$$

The thing to note about this result is that the photocurrent $q M A(f+g)$ is now amplified by $\beta_{F}$. In a photodiode there is no amplification and every photogenerated hole-electron pair results in at most only one $q$ of charge flowing through the device. The current through a phototransistor is $\beta_{F}$ times as large, so a phototransistor is $\beta_{F}$ times more "sensitive" than a photodiode.

We can think of the optical illumination as injecting majority carriers into the base of a phototransistor and thereby playing the same role as the base contact. In a common emitter connection we electrically force, or inject, carriers (current) into the base through the base contact; if the device is biased into its forward active region, the collector current is $\beta_{F}$ times as large. The same thing happens when we photoinject carriers into the base.

We can see from our results thus far that it does not matter which of the two junctions is illuminated. Nor do we need to illuminate both. These observations, combined with the physical reality of a practical bipolar transistor structure as illustrated in Fig. 8.1, (i.e., thin and spread out) lead to real phototransistors that look like the device illustrated in cross section in Fig. 8.31. The base-collector


FIGURE 8.31
Cross-sectional drawing of an npn bipolar phototransistor fabricated in silicon using a planar process.


FIGURE 8.32
(a) Circuit schematic for a phototransistor like that of Fig. 8.31, in which the nature of the device as a photodiode merged with a transistor is highlighted; (b) circuit schematic for a phototransistor in which the photodiode in (a) is represented as an independent current source.
junction is made as large as necessary to collect the incident signal, and the emitter-base junction is kept small to block as little of the lower junction as practical. Built this way, of course, the device even physically looks very much like a photodiode merged with a bipolar transistor into a composite device like that illustrated in Fig. 8.32a. The photodiode looks like a current source whose output provides the base current of the transistor; Fig. $8.32 b$ emphasizes this idea.

Phototransistors are used as sensors and detectors in many applications similar to those of photodiodes. It would also be tempting to think of using them in solar cell applications if we could get $\beta_{F}$ times the solar-generated current from them, but a little thought should convince you that such an approach is unsound. To get the gain of $\beta_{F}$ we needed to bias the transistor into its forward active region (i.e., add an external power source). The extra current and energy come from that source, not from the light, so the phototransistor is no better than a solar cell at converting optical energy to electrical energy.

### 8.4 SUMMARY

We began this chapter with a development of the Ebers-Moll model, a large-signal model for the terminal characteristics of a bipolar junction transistor. Although it is based upon a simplified one-dimensional approximation to a practical device structure, this model gives us excellent insight into the internal operation of bipolar transistors and provides important guidance in the design of these devices. We have introduced the concepts of the emitter, base, and collector defects and shown that the operation of the transistor is optimized by minimizing the emitter and base
defects. We have seen that this can be accomplished by keeping the base as thin as possible and by doping the emitter more heavily than the base, which is in turn more heavily doped than the collector.

We have pointed out that there are two types of bipolar transistors, $n p n$ and pnp, and we have developed Ebers-Moll models for both. We have seen that because the mobility of electrons is in general greater than that of holes, an $n p n$ bipolar transistor will have lower defects and higher gain than an equivalent $p n p$ device. This observation, along with observations that we will make in Chap. 14 concerning their higher speed, often make $n p n$ transistors the devices of choice, all else being equal.

After developing the basic Ebers-Moll model for the bipolar junction transistor and discussing its limitations, we considered approximations to this model in certain common operating regions, in particular in the forward active region. We have shown that the forward portion of the Ebers-Moll model dominates the transistor characteristics in the forward active region of operation and that in this region the model can be simplified considerably. We have also developed variants on this simplified model in which the base current is viewed as the signal that controls the collector current; the parameter of interest in this approach is the forward common-emitter current gain $\beta_{F}$, which we have shown can be made very large by minimizing the emitter and base defects.

We next developed linear equivalent circuit models for the terminal behavior of bipolar junction transistors. These models are useful for small-signal operation about fixed quiescent, or bias, points in the forward active region; we found that the parameter values in these models depend on the bias point chosen. We have developed models in both the common-emitter and common-base configurations and in which either the specific base current, the emitter current, or the baseemitter voltage was viewed as the input signal that controls the output signal, the collector current. We have seen that in all cases the small-signal models are the same for both $n p n$ and $p n p$ transistors.

We have argued that we could extend our transistor models, which were derived under quasistatic conditions, to high frequencies by adding the energy storage elements associated with each junction in the device. We have done this for our incremental models by adding a capacitor in parallel with the base-emitter junction to represent the diffusion and depletions charge stores associated with this junction in the forward active region (i.e., when it is forward-biased); we added a second capacitor in parallel with the base-collector junction to represent the depletion charge store of this junction, which is reverse-biased in the forward active region. The common-emitter small-signal high frequency model is called the hybrid- $\pi$ model and is used extensively in circuit analysis.

Finally, we have considered the optical excitation of a bipolar transistor. We have seen that the effect of light is to inject current into the base terminal and that this current will be amplified by the forward common-emitter current gain of the transistor, $\beta_{F}$, if it is biased in its forward active region. This process can be used very effectively as an optical light sensor, and bipolar transistors designed specifically to be sensitive to light are called phototransistors.

## PROBLEMS

8.1 The npn silicon transistor shown in Fig. P8.1 is characterized by the following parameters:
$N_{D E}=5 \times 10^{17} / \mathrm{cm}^{3}, w_{E}=3 \mu \mathrm{~m}, \tau_{h E}=0.1 \mu \mathrm{~s}, \mu_{h E}=250 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}$
$N_{A B}=5 \times 10^{16} / \mathrm{cm}^{3}, w_{B}=0.8 \mu \mathrm{~m}, \tau_{e B}=0.1 \mu \mathrm{~s}, \mu_{e B}=1000 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}$
$N_{D C}=5 \times 10^{15} / \mathrm{cm}^{3}, w_{C}=6 \mu \mathrm{~m}, \tau_{h C}=0.1 \mu \mathrm{~s}, \mu_{h C}=500 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}$
You must not assume that the lengths $w$ are small compared to the diffusion lengths. Instead, you will have to check this point and proceed accordingly. The active crosssectional area of the transistor is $5 \times 10^{-4} \mathrm{~cm}^{2}$. Use $k T / q=0.025 \mathrm{~V}$ and $n_{i}=$ $1.0 \times 10^{10} / \mathrm{cm}^{3}$.
(a) The transistor is operated in the forward mode with $v_{B E}>0$ and $v_{B C}=0$. Obtain. numerical values for the base and emitter defects, $\delta_{E F}$ and $\delta_{B F}$.
(b) Obtain numerical values for the corresponding defects, $\delta_{C R}$ and $\delta_{B R}$, when the transistor is operated in the reverse mode with $v_{B C}>0$ and $v_{B E}=0$.
(c) Obtain numerical values for $\beta_{F}$ and $\beta_{R}$.
(d) Obtain numerical values for the Ebers-Moll parameters: $I_{E S}, I_{C S}, \alpha_{F}, \alpha_{R}$.
(e) Show that your numerical calculations give $\alpha_{F} I_{E S}=\alpha_{R} I_{C S}$.
8.2 Two $n p n$ transistors, $Q_{A}$ and $Q_{B}$, are structurally identical in all respects except that the cross-sectional area of $Q_{B}$ is four times that of $Q_{A}$. These transistors are both biased in their forward active regions with $I_{C}=2 \mathrm{~mA}$ and $V_{C E}=6 \mathrm{~V}$.

The questions below concern the parameters in the Ebers-Moll and hybrid- $\pi$ models for these two devices. Indicate how each quantity specified compares for the larger transistor $Q_{B}$ and the smaller transistor $Q_{A}$. You may assume that spacecharge layer recombination is negligible and that the transistors are biased to operate under low-level injection conditions.
(a) Ebers-Moll emitter-base diode saturation current $I_{E S}$
(b) Ebers-Moll reverse alpha, $\alpha_{R}$
(c) Quiescent emitter-base voltage, $V_{E B}$
(d) Hybrid- $\pi$ transconductance, $g_{m}$
(e) Diffusion capacitance component $C_{e b}^{d f}$ of the hybrid- $\pi$ emitter-base capacitance $C_{\pi}$
(f) Hybrid- $\pi$ base-collector capacitance, $C_{\mu}$


FIGURE P8.1
8.3 Two high-gain bipolar transistors have identical dimensions and identical emitter, base, and collector doping profiles, except that transistor A is $n p n$ and transistor B is pnp. Indicate which device, if either, has the property stated below and explain why.
(a) Largest forward current gain $\beta_{F}$
(b) Smallest transconductance $g_{m}$ with $\left|I_{c}\right|=1 \mathrm{~mA}$
(c) Largest base-collector diode saturation current $I_{C S}$
(d) Lowest parasitic base resistance $r_{x}$
8.4 Consider an npn bipolar junction transistor, like that pictured in Fig. 8.2, that is fabricated of silicon and has the following doping levels and dimensions:

$$
\begin{array}{ll}
N_{D E}=5 \times 10^{18} \mathrm{~cm}^{-3}, & w_{E}^{*}=0.5 \mu \mathrm{~m} \\
N_{A B}=2 \times 10^{17} \mathrm{~cm}^{-3}, & w_{B}^{*}=0.2 \mu \mathrm{~m} \\
N_{D C}=5 \times 10^{15} \mathrm{~cm}^{-3}, & w_{C}^{*}=10 \mu \mathrm{~m}
\end{array}
$$

Assume that $\mu_{e}=1600 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}, \mu_{h}=600 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}, n_{i}=10^{10} \mathrm{~cm}^{-3}$, and $\tau_{\min }=10^{-4} \mathrm{~s}$. Assume also that the device is to be modeled using the Ebers-Moll formulation.
(a) What are the emitter, base, and collector defects in this device?
(b) What are $\alpha_{F}$ and $\alpha_{R}$ ?
(c) What are $J_{E S}$ and $J_{C S}$ ?
(d) Confirm that $\alpha_{F} J_{E S}=\alpha_{R} J_{C S}$
(e) What is $\beta_{F}$ ?
8.5 (a) For the bipolar transistor in Problem 8.1, calculate the emitter current density at the onset of high-level injection in the base, assuming that this corresponds to $n^{\prime}\left(0^{+}\right)=0.1 N_{A B}$.
(b) If the emitter, viewed from the top, is a rectangular stripe $3 \mu \mathrm{~m}$ wide and $L \mu \mathrm{~m}$ long, how large must $L$ be if this transistor is designed to operate at collector currents up to 2 mA without entering high-level injection?
(c) What is the incremental transconductance $g_{m}$ of this transistor with a quiescent collector current of 1 mA ?
(d) (i) Calculate the resistance of the base region (i.e., between $0^{+}$and $w_{B}^{-}$from long edge to long edge).
(ii) This type of transistor would typically be constructed with two base contact stripes on either side of the emitter stripe; each contact will supply half of the base current, which in turn flows at most halfway under the emitter (see


FIGURE P8.5

Fig. P8.5). Estimate the lateral voltage drop from the edge to the middle of the base region due to the base current when $I_{C}=1 \mathrm{~mA}$.
8.6 A lateral transistor has the structure illustrated in Fig P8.6a (the drawing is idealized and not to scale). Electrically this device can be modeled as a high $-\beta$ pnp transistor $Q$ with diodes $D_{S 1}$ and $D_{S 2}$ shunting the emitter-base and base-collector junctions. This question concerns the Ebers-Moll model for such a lateral pnp transistor. In answering parts a through c , ignore the space-charge layer widths. Also assume that one-dimensional models can be used for all of the junctions. Make appropriate engineering approximations.

The device dimensions and parameters are as follows:

$$
\begin{array}{clrl}
w_{p} & =w_{B}=1.0 \mu \mathrm{~m}, \quad L_{h B}=10 \mu \mathrm{~m}, & D_{e}=40 \mathrm{~cm}^{2} / \mathrm{s} \\
w_{S} & =100 \mu \mathrm{~m}, & w_{C}^{*}=w_{E}^{*}=5 \mu \mathrm{~m}, & D_{h}=15 \mathrm{~cm}^{2} / \mathrm{s}
\end{array}
$$

Areas of emitter and collector bottoms: $5 \times 10^{-2} \mathrm{~cm}^{2}$ (each)
Areas of emitter and collector sides: $10^{-2} \mathrm{~cm}^{2}$ (each)

$$
\begin{aligned}
& p^{+} \text {-regions: } p_{0}=5 \times 10^{18} \mathrm{~cm}^{-3} \\
& n \text {-region: } n_{0}=10^{16} \mathrm{~cm}^{-3}
\end{aligned}
$$

Use $n_{i}^{2}=1 \times 10^{20} \mathrm{~cm}^{-3}$.
(a) What are the numerical values of the saturation currents of the following diodes?
(i) The shunting diodes (i.e., the vertical diodes). Call this saturation current $I_{S S}$.
(ii) The Ebers-Moll model diodes of the high- $\beta$ pnp transistor (i.e., the lateral diodes). These are $I_{E S}$ and $I_{C S}$.
(b) Make an Ebers-Moll model valid for the composite transistor, that is, including the shunting vertical diodes (see Fig. P8.6b).
(i) What are $I_{E S}^{\prime}$ and $I_{C S}^{\prime}$ in terms of $I_{E S}, I_{C S}, I_{S S}, \alpha_{F}$, and $\alpha_{R}$ ?
(ii) What are $\alpha_{F}^{\prime}$ and $\alpha_{R}^{\prime}$ ?
(iii) Is $\beta_{F}^{\prime}$ greater than, equal to, or less than $\beta_{F}$ ?


FIGURE P8.6a


B

## FIGURE P8.6b

(c) Lateral transistors have symmetrical doping profiles and thus have $N_{A E}=$ $N_{A C} \gg N_{D B}$. Discuss the consequences of each of the following situations for transistor characteristics, and state whether they are desirable or not:
(i) $N_{A E} \gg N_{D B}$
(ii) $N_{A C} \gg N_{D B}$
8.7 Consider two bipolar junction transistors, an npn transistor and a pnp transistor. Both transistors have values of $\beta_{F}=200$ and $\beta_{R}=20$ and have comparable values of $I_{E S}$.
(a) What is the numerical value of the ratio $I_{C S} / I_{E S}$ for each transistor?

Assume that there is negligible recombination in the base regions of these devices. In both transistors, the current crossing the emitter-base junction consists of both electrons and holes.
(b) Find the numerical value for the fraction of the emitter current carried by electrons in the $n p n$ transistor and by holes in the $p n p$.
These transistors are used in the circuit illustrated in Fig. P8.7. Assume that the npn transistor is operating in the forward active region.


## FIGURE P8.7



FIGURE P8.8
(c) Determine the region of operation of the $p n p$ transistor, and briefly justify your choice. Your choice should be one of the following: forward active, reverse active, saturation, or cutoff.
8.8 For each of the transistor circuits shown in Fig. P8.8, sketch the excess minority carrier distribution through the device. For each transistor, $\beta_{F}=100, V_{B E, O N}=0.6$ V , and $\bar{N}_{D E}=4 N_{A B}=16 N_{D C}$. Assume infinite minority carrier lifetimes and $W_{E}=W_{B}=0.2 W_{C}$.
8.9 Consider designing an integrated circuit according to the following simplified design rules:

Minimum oxide opening that can be etched:
Minimum-width line (opening or feature) that can be defined:
Minimum separation between metal lines:
$1 \mu \mathrm{~m}$ by $1 \mu \mathrm{~m}$
M $1 \mu \mathrm{~m}$
Minimum nesting allowance, i.e., contact opening within a diffusion, metal pattern overlap of a contact opening, etc.:
$2 \mu \mathrm{~m}$ all around
(a) Lay out a bipolar transistor like that pictured in Fig. 8.1 with the smallest emitter possible under these design rules. Use a rectangular, rather than circular, geometry.
(b) Calculate the approximate ratio of the area of the base-collector junction to that of the emitter-base junction, and discuss the implications of this for $C_{\pi}$ and $C_{\mu}$. Assume a base-collector junction depth below the top wafer surface of $0.5 \mu \mathrm{~m}$ and an emitter-base junction depth of $0.3 \mu \mathrm{~m}$; also assume that a diffusion through an oxide opening spreads laterally 80 percent of the junction depth.
8.10 This question concerns an $n p n$ bipolar transistor that has the following dimensions and properties:

$$
\begin{gathered}
N_{D E}=2 N_{A B}=4 N_{D C}, \quad D_{e}=2 D_{h} \\
w_{E}^{*}=w_{B}^{*}=w_{e}^{*}=W, \quad L_{e}=L_{h}=10 W
\end{gathered}
$$

(a) Based on the emitter-base junction, what is the ratio of hole to electron current crossing this junction in forward bias?
(b) What fraction of the electrons flowing from from the emitter into the base when the base-emitter junction is forward biased recombine in the base?
(c) Suppose you want to change the dopant densities in this transistor to improve its forward active region characteristics. Assuming $N_{A B}$ is fixed, what would you do to $N_{D E}$ and $N_{D C}$, and why?
8.11 A certain one-dimensional $n p n$ bipolar transistor has $N_{D E}=2 N_{A B}=4 N_{D C}$ and $W_{E}=W_{B}=0.25 W_{C}$. Throughout it the minority carrier lifetime is infinite and $\mathrm{D}_{\mathrm{e}}=2.5 \mathrm{D}_{\mathrm{h}}$. This transistor can be connected in five different ways to make a p-n diode, as illustrated in Fig. P8.11.

(a)

(b)

(c)

(d)

(e)

FIGURE P8.11




FIGURE P8. 12

For the same value of $V_{D}$, given that $V_{D} \gg k T / q$, sketch the excess minority carrier distribution in the device in each connection.
8.12 Consider using the emitter-base junction of an $n p n$ transistor as a diode. We want to compare the three possible connections illustrated in Fig. P8.12. Assume $\mathrm{D}_{\mathrm{e}}=2.5 \mathrm{D}_{\mathrm{h}}$.
(a) (i) Find a relationship for $i_{D}$ as a function of $v_{A B}$ in terms of the Ebers-Moll parameters ( $\alpha_{F}, \alpha_{R}, I_{E S}$, and $I_{C S}$ ) of the transistor.
(ii) For which of these "diodes" is " $I_{S}$ " largest? Smallest?
(b) For each of these connections find expressions in terms of the Ebers-Moll parameters for the ratio of the collector current in the transistor to the emitter current.
(c) Indicate on sketches of each of the connections the main current path through the device from $A$ to $B$.
(d) Sketch the excess hole and electron distributions through this transistor in each of the connections. Assume that $N_{D E}=2 N_{A B}=4 N_{D C}$, and $W_{E}=W_{B}=0.5 W_{C}$. Assume infinite lifetimes.
(e) (i) In which of these diode connections is the total density of excess minority carriers under forward bias the smallest, assuming the same applied voltage $v_{D}$, and why?
(ii) In which of these diode connections is the total density of excess minority carriers under forward bias the smallest, assuming the same total current $i_{D}$, and why?
(iii) In which connection is the diffusion capacitance largest, assuming the same voltage bias $V_{D}$, and why?
8.13 A: pnpitransistor with $\beta_{F}=200$ and $\beta_{R}=1$ is used as a switch in the circuit shown in Fig. P8.13. For this application it is important to know the collector current


FIGURE P8.13
when the switch is in the "off" state. The switch can be turned "off" in a number of different ways: (a) by opening the base lead, thereby reducing $i_{B}$ to 0 ; (b) by grounding the base; (c) by applying a large reverse bias between base and ground. The collector current for each of these cases is defined as
(a) $I_{C E O}$ : collector current with base open
(b) $I_{C E S}$ : collector current with base short-circuited
(c) $I_{C E X}$ : collector current with large reverse bias from base to emitter Find numerical values for each of these currents when $I_{C S}=10 \mathrm{nA}$.

## CHAPTER 9

## THE MOS CAPACITOR

In modern semiconductor electronics there are a number of fundamental structures, including the $p-n$ junction, the metal-semiconductor contact, and the metal-oxidesemiconductor capacitor. We discussed p-n junctions in Chaps. 6 and 7, and Appendix E deals with metal-semiconductor contacts. In this chapter we focus our attention on the metal-oxide-semiconductor (MOS) capacitor structure.

The MOS capacitor forms the heart of an important family of devices called MOS field effect transistors, or MOSFETs. In much the same way that understanding $p-n$ junctions is central to understanding the operation of bipolar junction transistors, understanding the MOS capacitor is central to understanding the operation of MOSFETs. The MOS capacitor is also a useful device in its own right (i.e., as a capacitor), and the MOS capacitor structure is also useful as an optical sensor.

We will begin our study of the MOS capacitor in this chapter by looking at this structure in thermal equilibrium. We will then study what happens when we apply voltage to an MOS capacitor and look at the unique features that make the MOS capacitor so useful in devices.

### 9.1 THE MOS CAPACITOR IN THERMAL EQUILIBRIUM

To form an MOS capacitor we start with a sample of uniformly doped semiconductor, say $p$-type silicon, with an ohmic contact on one side. The other side is covered with a thin insulating layer, in the case of silicon this is usually silicon dioxide, $\mathrm{SiO}_{2}$, or a combination of silicon dioxide and silicon nitride, $\mathrm{Si}_{3} \mathrm{~N}_{4}$. A thin film of metal-aluminum is a common example-deposited on this insula-
tor completes the metal-oxide-semiconductor capacitor structure. Such an MOS capacitor is illustrated in Fig. 9.1.

Now consider the electrostatic potential variation through this structure, assuming thermal equilibrium. Assume for simplicity that the ohmic contact is also made of aluminum, as in fact it often is. As we have done before, we will begin by considering variation only in one dimension, the $x$-direction, which in this case we will take to be normal to the silicon surface, as illustrated in Fig. $9.2 a$. The potential in the aluminum relative to intrinsic silicon is $\phi_{\mathrm{Al}}$, and that of $p$-type silicon is $\phi_{p}$. The thickness of the silicon dioxide is $t_{o}$. If the silicon dioxide can be modeled as a perfect dielectric and if there are no ions in it or at any of the interfaces, the potential profile must look like the plot in Fig. 9.2b. The two aluminum contacts are assumed to be shorted together as shown in Fig. $9.2 a$, and the structure is assumed to be in thermal equilibrium, so the net change in potential going around the circuit is zero. Because the potential in the metal is higher than that in the semiconductor, there must be a slight depletion in the semiconductor at each surface (i.e., at $x=0$ and at $x=w$ ) and an excess of positive charge in the metal. The potential profile and net charge distribution are illustrated in Figs. $9.2 b$ and $c$, respectively.

Your attention should be focused on the metal-oxide-semiconductor structure on the left of Fig. 9.2a, rather than on the contact structure on the right. We will assume that the contact to the silicon on the right performs like an ideal ohmic contact. All of the "action" is on the left.

The structure, as you can see, is relatively simple. Although we have yet to quantify our description, you should be comfortable with these pictures after having studied $p-n$ junctions in Chap. 7.

### 9.2 ISOLATED MOS CAPACITOR WITH APPLIED VOLTAGE

Given our qualitative picture of what an MOS capacitor looks like in thermal equilibrium, let us now open the circuit and apply an external voltage source between the two terminals. We will discuss what happens qualitatively as well as develop a quantitative model based on the depletion approximation.


FIGURE 9.1
Typical MOS capacitor formed of aluminum, silicon dioxide, and p-type silicon.


FIGURE 9.2
(a) One-dimensional MOS capacitor structure with its terminals shorted and in thermal equilibrium; (b) the variation in the electrostatic potential relative to intrinsic silicon through this structure; and (c) the corresponding net charge distribution.

### 9.2.1 Flat-band

Consider first applying a voltage $v_{G B}$ to the left-hand capacitor electrode, which we label G for "gate," relative to the ohmic contact, which we label B for "back," that is negative. The potential at the interface between the oxide and the semiconductor, $\phi(0)$, decreases toward $\phi_{p}$, and the depletion region width also decreases. At the same time the positive charge is removed from the capacitor electrode (i.e., at $x=-t_{0}$ ). For some particular applied voltage, there will be no depletion of the semiconductor and the potential at the surface of the semiconductor will equal that in its bulk [i.e., $\phi(0)=\phi_{p}$ ]. This situation, illustrated in Figs. $9.3 a$ and $b$, is called the flatband condition, and the corresponding applied voltage $V_{\mathrm{FB}}$ is an important
point of reference. For the flat-band condition the potential difference across the oxide is also zero because there is no net charge anywhere in the structure. The flat-band voltage is thus

$$
\begin{equation*}
V_{\mathrm{FB}}=-\left(\phi_{m}-\phi_{p}\right) \tag{9.1}
\end{equation*}
$$

where $\phi_{m}$ is the electrostatic potential of the metal relative to intrinsic silicon. This is illustrated in Fig. 9.3a.

(a)

(c)

(e)

(b)

(d)

(f)

FIGURE 9.3(a-f)
Electrostatic potential and net charge distributions for an MOS structure on a p-type semiconductor under various bias conditions, assuming that the depletion approximation is valid: $(a$ and $b)$ flat-band, $v_{G B}=V_{F B} ;(c$ and $d)$ accumulation, $v_{G B}<V_{\mathrm{FB}}$; $(e$ and $f)$ depletion, $V_{\mathrm{FB}}<v_{G B}<V_{T} ;(g$ and $h)$ threshold, $v_{G B}=V_{T} ;(i$ and $j)$ inversion, $v_{G B}>V_{T}$.


FIGURE 9.3(g-j)
(continued)

### 9.2.2 Accumulation

If we apply a voltage more negative than $V_{\mathrm{FB}}$, the electrostatic potential in the semiconductor decreases, the hole density at the surface increases rapidly, and all of the additional field is terminated on a thin layer of holes that accumulates in the semiconductor within a few nanorneters of the interface. This condition is called accumulation and is illustrated in Figs. $9.3 c$ and $d$. Assuming that all of the accumulated holes are right at the interface, we can write the resulting charge density using

$$
\begin{equation*}
v_{G B}-V_{\mathrm{FB}}=-\frac{q_{A}^{*} t_{0}}{\varepsilon_{0}} \tag{9.2}
\end{equation*}
$$

so that we have

$$
\begin{equation*}
q_{A}^{*}=-\left(v_{G B}-V_{\mathrm{FB}}\right) \frac{\varepsilon_{o}}{t_{0}} \tag{9.3}
\end{equation*}
$$

Remember that $v_{G B}-V_{\mathrm{FB}}$ is negative, so $q_{A}^{*}$ is positive. In this model, the charge density $\rho(x)$ is a spatial charge impulse of intensity $q_{A}^{*} \mathrm{C}$ per $\mathrm{cm}^{2}$ at $x=0$ :

$$
\begin{equation*}
\rho(x)=q_{A}^{*} \delta(x) \quad\left[\left(\mathrm{C} / \mathrm{cm}^{2}\right)\right] \tag{9.4}
\end{equation*}
$$

as illustrated in Fig. 9.3d.

### 9.2.3 Depletion

If we next apply a voltage greater than $V_{F B}$, we must induce negative charge in the semiconductor, which implies (at least initially) that we deplete the surface, exposing fixed, negatively charged ionized acceptors, as illustrated in Figs. 9.3e and $f$. Some of the applied voltage in excess of $V_{F B}$ falls across the oxide, and some appears in the semiconductor across the depletion region, as Fig. $9.3 e$ illustrates. The potential drop across the oxide is ( $v_{G B}-V_{\mathrm{FB}}$ ) less the potential drop in the semiconductor, $\phi(0)-\phi_{\rho}$. It is also equal to the negative of the depletion region charge of the semiconductor, which we will call $q_{D}^{*}$, divided by the capacitance per unit area of the oxide, $\varepsilon_{0} / t_{0}$. Thus we can write

$$
\begin{equation*}
\left(v_{G B}-V_{\mathrm{FB}}\right)-\left[\phi(0)-\phi_{p}\right]=-q_{D}^{*} \frac{t_{0}}{\varepsilon_{0}} \tag{9.5}
\end{equation*}
$$

But $q_{D}^{*}$ can also be related to the change in the electrostatic potential in the semiconductor. Using the depletion approximation and assuming that the width of the depletion region is $x_{D}$, we assume that

$$
\rho(x)= \begin{cases}-q N_{A} & \text { for } 0 \leq x \leq x_{D}  \tag{9.6}\\ 0 & \text { for } x \geq x_{D}\end{cases}
$$

Thus

$$
\begin{equation*}
q_{D}^{*}=-q N_{A} x_{D} \tag{9.7}
\end{equation*}
$$

The electric field must then be given by

$$
\mathscr{E}(x)= \begin{cases}-\frac{q N_{A}\left(x-x_{D}\right)}{\varepsilon_{S i}} & \text { for } 0 \leq x \leq x_{D}  \tag{9,8}\\ 0 & \text { for } x \geq x_{D}\end{cases}
$$

and the electrostatic potential must be

$$
\phi(x)= \begin{cases}\frac{q N_{A}\left(x-x_{D}\right)^{2}}{2 \varepsilon_{S i}}+\phi_{p} & \text { for } 0 \leq x \leq x_{D}  \tag{9.9}\\ \phi_{p} & \text { for } x \geq x_{D}\end{cases}
$$

Thus

$$
\phi(0)=\frac{q N_{A} x_{D}^{2}}{2 \varepsilon_{\mathrm{Si}}}+\phi_{p}
$$

or

$$
\begin{equation*}
x_{D}=\sqrt{\frac{2 \varepsilon_{S i}\left[\phi(0)-\phi_{p}\right]}{q N_{A}}} \tag{9.10}
\end{equation*}
$$

and

$$
\begin{equation*}
q_{D}^{*}=-\sqrt{2 \varepsilon_{\mathrm{Si}} q N_{A}\left[\phi(0)-\phi_{p}\right]} \tag{9.11}
\end{equation*}
$$

Using Eqs. (9.5) and (9.11), we can solve for $\phi(0)$ in terms of $v_{G B}$, so we can find $x_{D}$ and $q_{D}^{*}$ if we so desire.

Clearly, as the applied voltage increases, the depletion width in the semiconductor increases and the electrostatic potential at the oxide-semiconductor interface, $\phi(0)$, increases.

As the electrostatic potential in the semiconductor changes, the hole and electron populations also change. We already used this fact without making note of it when we used the depletion approximation. That is, just as when we treated an abrupt $p-n$ junction in Chap. 6, we implicitly argue above that as the potential increases above $\phi_{p}$ for $x \leq x_{D}$, the mobile hole population decreases rapidly and the net charge density increases rapidly with $x$ to $-q N_{A}$. Before going further, we must question our assumption that the carrier populations are still related to the electrostatic potential as they are in thermal equilibrium. Specifically, is it still valid to use the thermal equilibrium expressions

$$
\begin{gather*}
n_{o}(x)=n_{i} e^{q \phi(x) / k T}  \tag{6.7}\\
p_{o}(x)=n_{i} e^{-q \phi(x) / k T} \tag{6.8}
\end{gather*}
$$

when we have voltage applied to an MOS capacitor?
The answer is yes in the present situation, because in the steady state there is no current flowing through the structure and the semiconductor remains in thermal equilibrium. In the steady state, the source providing the applied voltage $v_{G B}$ supplies no energy to the system and both the electron and hole currents are zero. If that is the case we again arrive at Eqs. (6.1), which led to the expressions above.

Now we can see another important consequence of the increase in electrostatic potential in the semiconductor, in addition to the decrease in hole concentration $p(x)$, for $0 \leq x \leq x_{D}$; namely, that the electron population increases. The density stays low and the negative charge density due to electrons, $-q n(x)$, is negligible compared to that due to fixed ionized acceptors, $-q N_{A}$, until the electrostatic potential, $\phi$, approaches $-\phi_{p}$. When $\phi(x) \approx-\phi_{p}$, however, $n(x) \approx$ $N_{A}$ and the electrons can no longer be ignored. This occurs first at the oxidesemiconductor interface. We call the applied voltage for which $\phi(0)=-\phi_{p}$ the threshold voltage $V_{T}$.

### 9.2.4 Threshold and Inversion

The threshold voltage $V_{T}$ is defined as $v_{G B}$ such that $\phi(0)=-\phi_{p}$. Using Eqs. (9.10) and (9.11) we can thus write

$$
\begin{equation*}
X_{D T}=\sqrt{\frac{2 \varepsilon_{\mathrm{Si}}\left|2 \phi_{p}\right|}{q N_{A}}} \tag{9.12}
\end{equation*}
$$

and

$$
\begin{equation*}
Q_{D T}^{*}=-\sqrt{2 \varepsilon_{\mathrm{Si}} q N_{A}\left|2 \phi_{p}\right|} \tag{9.13}
\end{equation*}
$$

where a subscript T has been added to denote threshold values and capital $X$ and $Q$ are used to emphasize that these are special values. The situation in the semiconductor when $v_{G B}=V_{T}$, a situation we describe as "being at threshold" is illustrated in Figs. 9.3 g and $h$.

By using this last result in Eq. (9.5) we can obtain

$$
\begin{equation*}
V_{T}=V_{\mathrm{FB}}-2 \phi_{p}+\frac{t_{0}}{\varepsilon_{o}} \sqrt{2 \varepsilon_{\mathrm{Si}} q N_{\mathrm{A}}\left|2 \phi_{p}\right|} \tag{9.14}
\end{equation*}
$$

For $V_{\mathrm{FB}} \leq \nu_{G B} \leq V_{T}$ the depletion approximation model described in Sec. 9.2 .3 is appropriate, but for $v_{G B} \geq V_{T}$ we use a different model. The electron density near the oxide-semiconductor interface increases exponentially with the electrostatic potential $\phi$, so once it equals and surpasses $N_{A}$, the electrons will become the dominant source of new negative charge induced in the semiconductor by further increases in applied voltage. A slight increase in $\phi(0)$ above $-\phi_{p}$ increases $n(0)$ dramatically (i.e., exponentially).

Rather than try to calculate $n(x)$ for $x \geq 0$, we argue that all of these induced electrons will be in a very thin layer near the surface, which we treat spatially as an impulse of negative charge $q_{N}^{*}$ at $x=0$. Thus, above threshold (i.e., for $v_{G B}>V_{T}$ ) we approximate the net charge distribution in the semiconductor as

$$
\rho(x)= \begin{cases}q_{N}^{*} \delta(x)-q N_{A} . & \text { for } 0 \leq x \leq X_{D T}  \tag{9.15}\\ 0 & \text { for } x \geq X_{D T}\end{cases}
$$

Notice that we have assumed further that the depletion region width does not increase above threshold, neither does $\left|q_{D}^{*}\right|$. We know that the electrostatic potential must increase slightly over a shallow distance near the oxide-semiconductor interface, but we assume that this leads to a negligible increase in the depletion region width and thus in $\left|q_{D}^{*}\right|$. All of the action, if you will, above threshold is near the interface.

The situation at the interface above threshold is analogous to what it was for accumulation, except that now we have a high density of mobile electrons rather than mobile holes. A thin surface layer has been created in which the majority carriers are electrons. This pseudo-n-type layer is called a channel, or inversion layer. The surface is said to be inverted (from $p$-type to $n$-type), and this condition is called inversion. This situation is summarized in Figs. $9.3 i$ and $j$.

The sheet charge density in the channel, $q_{N}^{*}$, is a very important quantity. We can calculate it because, as we have said, it is induced by the applied voltage in excess of threshold. Thus,

$$
\begin{equation*}
q_{N}^{*}=-\left(v_{G B}-V_{T}\right) \frac{\varepsilon_{o}}{t_{o}} \tag{9.16}
\end{equation*}
$$

when $v_{G B} \geq V_{T}$.

## Example

Question. Consider an MOS capacitor fabricated on a $p$-type silicon substrate that is doped with a net acceptor concentration $N_{A}$ of $2 \times 10^{16} \mathrm{~cm}^{-3}$. The electrostatic potential in the gate metal relative to intrinsic silicon, $\phi_{m}$, is +0.3 V ; and the gate dielectric is silicon dioxide 25 nm thick. The relative dielectric constant of silicon dioxide is 3.9 , and that of silicon is 11.7 . What are the flat-band and threshold voltages, $V_{\mathrm{FB}}$ and $V_{T}$, respectively; what are the width of the depletion region above threshold, $X_{D T}$, and the sheet charge density in the depletion region above threshold, $Q_{D T}^{*}$; and what is the sheet charge density in the inversion layer, $q_{N}^{*}$, when the gate voltage $v_{G B}$ is 2 V greater than the threshold voltage $V_{T}$ ? Assume room temperature, and take $n_{i}$ to be $10^{10} \mathrm{~cm}^{-3}$ and $k T / q$ to be 0.025 V .

Discussion. We first calculate the electrostatic potential $\phi_{p}$ in the bulk of the $p$-type silicon substrate. Using Eq. (6.26b), we find that $\phi_{p}$ is -0.35 V . Thus, from Eq. (9.1), we find that $V_{\mathrm{FB}}$ is -0.65 V .

To find the threshold voltage, we use Eq. (9.14) and find that $V_{T}$ is approximately 0.53 V .

To calculate the maximum depletion region width, $X_{D T}$, we use Eq. (9.12) and calculate that it is approximately $0.2 \mu \mathrm{~m}$. The corresponding sheet charge density in the depletion region, $Q_{D T}^{*}$, is $-1.34 \times 10^{-8} \mathrm{C} / \mathrm{cm}^{2}$.

Finally, using Eq. (9.16) we calculate that with the gate biased in excess of threshold, the sheet charge density in the inversion layer, $q_{N}^{*}$, is $-2.8 \times 10^{-7} \mathrm{C} / \mathrm{cm}^{2}$. This corresponds to a sheet electron density of $1.7 \times 10^{12} \mathrm{~cm}^{-2}$.

### 9.3 BIASED MOS CAPACITOR WITH CONTACT TO THE CHANNEL

The $n$-type inversion layer that forms under an MOS capacitor structure on a $p$-type semiconductor can be thought of as an $n$-type surface layer. Thinking this way we can see that we have effectively formed a $p-n^{+}$junction at the surface. Thus far in our discussion, the semiconductor has been in thermal equilibrium throughout, including up to the oxide-semiconductor interface, and so this junction is also in equilibrium (i.e., zero-biased). Imagine, however, that we can make electrical contact to the $n$-side of this junction and reverse-bias it by increasing the potential on that side relative to the $p$-side. No appreciable current will flow, but the potential drop across the depletion region will increase and the depletion region width will increase above the value $X_{D T}$ specified in Eq. (9.12). Clearly $q_{D}^{*}$ will change, and as a consequence $q_{N}^{*}$ will also change, assuming that the voltage on the top metal electrode, $v_{G B}$, is held fixed. These effects are very important in field effect transistors that use MOS capacitors, so we will consider them in more detail now. First we will assume that we somehow have direct electrical contact to the channel as we have just argued; then we will assume that we get access to the channel through a heavily doped $n$-region next to the MOS capacitor.

### 9.3.1 Direct Contact to the Channel

To model the changes that occur when we can apply a voltage on the channel relative to the semiconductor bulk, let us assume that we can have direct electrical
contact to the $n$-type inversion-layer side of our induced $p-n$ diode such that we can apply a voltage $v_{C B}$ to the channel, relative to the back contact, where $v_{C B} \geq 0$. We assume that all of this applied reverse bias (remember that our positive reference is now the $n$-side of the diode) appears across the depletion region. The change in electrostatic potential across this region is now $-2 \phi_{p}+v_{C B}$ rather than simply $-2 \phi_{p}$, so the depletion region becomes

$$
\begin{equation*}
X_{D T}\left(v_{C B}\right)=\sqrt{\frac{2 \varepsilon_{\mathrm{Si}}\left(\left|2 \phi_{p}\right|+v_{C B}\right)}{q N_{A}}} \tag{9.17}
\end{equation*}
$$

and the depletion layer charge is

$$
\begin{equation*}
Q_{D T}^{*}\left(v_{C B}\right)=-\sqrt{2 \varepsilon_{S i} q N_{A}\left(\left|2 \phi_{p}\right|+v_{C B}\right)} \tag{9.18}
\end{equation*}
$$

The sheet mobile charge density in the inversion layer, $q_{N}^{*}$, is found by calculating the change in potential across the oxide and setting it equal to ( $q_{N}^{*}+$ $\left.Q_{D T}^{*}\right) t_{o} / \varepsilon_{o}$. Because we know $Q_{D T}^{*}$ from Eq. (9.18), we can calculate $q_{N}^{*}$. The potential change across the oxide must be the total potential difference between the gate electrode and the quasineutral region $\left(x>X_{D T}\right)$, which is $v_{G B}-V_{F B}$, less the potential change across the depletion region, which is $\left|2 \phi_{p}\right|+v_{C B}$. Thus we must have

$$
v_{G B}-V_{\mathrm{FB}}-\left|2 \phi_{p}\right|-v_{C B}=-\frac{t_{o}}{\varepsilon_{o}}\left[q_{N}^{*}\left(v_{C B}\right)+Q_{D T}^{*}\left(v_{C B}\right)\right]
$$

Solving this for $q_{N}^{*}$ yields

$$
\begin{equation*}
q_{N}^{*}\left(v_{C B}\right)=-\frac{\varepsilon_{o}}{t_{0}}\left[v_{G B}-V_{\mathrm{FB}}-\left|2 \phi_{p}\right|-v_{C B}\right]+Q_{D T}^{*}\left(v_{C B}\right) \tag{9.19}
\end{equation*}
$$

where $Q_{D T}^{*}$ is given by Eq. (9.18), and we assume that $v_{G B} \geq V_{F B}+\left|2 \phi_{p}\right|+v_{C B}$.
These results are summarized in Fig. 9.4, which compares the electrostatic potential and net charge density profiles through an MOS capacitor with $\nu_{C B}=0$ and with $v_{C B}>0$.

It is worth noticing that when $v_{C B}>0$, the inversion layer charge $q_{N}^{*}$ can be zero even though $v_{G B}$ is greater than the $V_{T}$ specified in Eq. (9.14). That is, the threshold voltage is now increased by the presence of $v_{C B}$ to a value of

$$
\begin{equation*}
V_{T}\left(v_{C B}\right)=V_{\mathrm{FB}}+\left|2 \phi_{p}\right|+v_{C B}-\frac{t_{o}}{\varepsilon_{o}} Q_{D T}^{*}\left(v_{C B}\right) \tag{9.20}
\end{equation*}
$$

This makes sense physically because the depletion region is wider, which in turn means that there is more voltage drop both across it and, because $q_{D T}^{*}$ is larger, across the oxide. Clearly the voltage $v_{G B}$ that must be applied to invert the surface and create or sustain the channel must be larger.

Finally, note that Eq. (9.16) for the channel charge density above threshold is still valid if the appropriate expression, Eq. (9.20), is used for the threshold voltage.



FIGURE 9.4
Profiles throughout an MOS capacitor above threshold for two different channel bias conditions: (a) the electrostatic potential; (b) the net charge density. (The dashed plots are for no voltage applied to the channel, $v_{C B}=0$, and the solid plots are for reverse bias on the channel, $v_{C B}>0$, relative to the $p$-region, or "substrate.")


FIGURE 9.5
MOS capacitor on a p-type silicon sample, or "substrate" with heavily doped $n$-type regions adjacent to the ends of the channel.

### 9.3.2 Adjacent $p$ - $n$ Junction

As a practical matter, electrical contact to an inversion layer is generally made through an adjacent heavily doped region of the same type as the inversion layer (e.g., $n$-type in the structure we have been discussing). An example is illustrated in Fig. 9.5. When the region under the gate electrode $G$ is inverted, we assume that there is little or no barrier to electron motion from the $n^{+}$-regions to the inversion layer and vice versa. Thus the channel and the $n^{+}$-regions are all at the same potential; therefore $v_{C B}=v_{S B}$. Notice that we label the contact on the $n^{+}$-regions with an $S$, which stands for "source." This name comes from the fact that in this structure the $n^{+}$-regions are the origin, or source, of the electrons that form the inversion layer.

In the next chapter we will consider what happens when the two $n^{+}$-regions on either side of the gate electrode are not at the same potential. We will see that there will be a gradient in potential in the channel, moving from left to right. A gradient in potential implies an electric field, which will in turn drift the carriers in the channel (electrons in this case) from one $n^{+}$-electrode to the other. Clearly the amount of motion (i.e., the drift current) will depend on the amount of charge and thus on the gate voltage. The gate can therefore be used to control the current between the two $n^{+}$-regions. This phenomenon will form the basis for the MOS field effect transistor that we will introduce in Chap. 10.

### 9.4 CAPACITANCE OF MOS CAPACITORS VERSUS BIAS

We call the metal-oxide-semiconductor "sandwich" that we have been discussing an MOS capacitor, but we have not yet looked explicitly at its capacitance, that is, at how the charge stored in this structure varies with the voltage applied to it. This issue is very interesting and provides us with an important tool for understanding and characterizing MOS capacitors.

We will take the charge stored on an MOS capacitor to be the charge on the gate electrode, which we call $q_{G}$. We envision a structure like that shown in Fig. 9.5, with $v_{B S}=0$, and ask how $q_{G}$ varies with $v_{G S}$. As you may already realize, and as we shall show shortly, $q_{G}$ is a nonlinear function of $v_{G S}$, so we cannot model this charge store as a linear capacitor. We can, however, define a capacitance for the structure that relates incremental changes in the stored charge to incremental changes in the gate voltage. This capacitance will clearly be a function of the quiescent gate voltage. We define it as

$$
\begin{equation*}
\left.C_{g S}\left(V_{G S}, 0\right) \equiv \frac{\partial q_{G}}{\partial v_{G S}}\right|_{v_{G S}=V_{G S}, v_{B S}=0} \tag{9.21}
\end{equation*}
$$

Thus for small voltage deviations away from $V_{G S}$ (i.e., if $v_{G S}$ is $V_{G S}+v_{g s}$ ), the charge on the gate, $q_{G}$, will be given approximately by

$$
\begin{equation*}
q_{G}=Q_{G}+q_{g} \approx Q_{G}+C_{g s} v_{g s} \tag{9.22}
\end{equation*}
$$

We next use our discussion from Secs. 9.2 and 9.3 to obtain expressions for $q_{G}$ in each of the three bias regions of an MOS capacitor (accumulation, depletion, and inversion). We will calculate $C_{g s}$ in each of these regions. We continue to assume that we have an MOS structure fabricated on a $p$-type semiconductor; assume further that the gate electrode is $L$ units long and $W$ units wide.

Beginning with accumulation, we see from Fig. $9.3 d$ that $q_{G}$, the charge on the gate at $x=-t_{0}$, is simply $-q_{A}^{*} L W$, which, using Eq. (9.3) and recalling that $v_{G B}=v_{G S}$, gives us

$$
\begin{equation*}
q_{G}=L W \frac{\varepsilon_{o}}{t_{o}}\left(v_{G S}-V_{\mathrm{FB}}\right) \tag{9.23a}
\end{equation*}
$$

It is convenient at this point to define the factor $\varepsilon_{o} / t_{o}$ as the oxide capacitance per unit area, $C_{o x}^{*}$, so that we write

$$
\begin{equation*}
q_{G}=L W C_{\mathrm{ox}}^{*}\left(v_{G S}-V_{\mathrm{FB}}\right) \tag{9.23b}
\end{equation*}
$$

Applying the definition of gate capacitance, Eq. (9.21), we find that in accumulation (i.e., for $v_{G S} \leq V_{F B}$ ) we have

$$
\begin{equation*}
C_{g s}\left(V_{G S} \leq V_{\mathrm{FB}}\right)=L W C_{\mathrm{ox}}^{*} \tag{9.24}
\end{equation*}
$$

This result makes perfect sense. In accumulation, charge is stored on either side of the oxide just as it is in a metal plate capacitor, and the capacitance of such a structure is its area $L W$ multiplied by the dielectric constant of the insulator, $\varepsilon_{0}$, divided by the plate spacing $t_{0}$.

Moving next to biases in depletion, we can refer to Fig. 9.3f, where we see that $q_{G}$, the charge on the gate at $x=-t_{o}$, is $q N_{A} x_{D} L W$, which is also $-q_{D}^{*} L W$. We did not obtain an expression for either $x_{D}$ or $q_{D}^{*}$ as a function of the gate voltage in Sec. 9.2, so we need to do so now in order to see how $q_{G}$ varies with $v_{G S}$ and to calculate $C_{g s}$. To proceed we solve Eq. (9.5) for $\left[\phi(0)-\phi_{p}\right]$
and substitute it into Eq. (9.11). This yields a quadratic equation for $q_{D}^{*}$ that we can solve. Doing so yields

$$
\begin{equation*}
q_{D}^{*}=-\frac{\varepsilon_{\mathrm{Si}} q N_{A}}{C_{0 \mathrm{x}}^{*}}\left(\sqrt{1+\frac{2 C_{0 \mathrm{o}}^{*}{ }^{2}\left(v_{G S}-V_{\mathrm{FB}}\right)}{\varepsilon_{S \mathrm{i}} q N_{A}}}-1\right) \tag{9.25}
\end{equation*}
$$

We have already pointed out that $q_{G}=-q_{D}^{*} L W$, so we arrive at

$$
\begin{equation*}
q_{G}=L W \frac{\varepsilon_{\mathrm{Si}} q N_{A}}{C_{\mathrm{ox}}^{*}}\left(\sqrt{1+\frac{2 C_{\mathrm{ox}}^{*}{ }^{2}\left(v_{G S}-V_{\mathrm{FB}}\right)}{\varepsilon_{S \mathrm{~S}} q N_{A}}}-1\right) \tag{9.26}
\end{equation*}
$$

This expression is not terribly instructive at this point, but it does show us that $q_{G}$ varies as the square root of ( $v_{G S}-V_{F B}$ ), which reflects the depletion region increase with $v_{G S}$. Note also that when $v_{G S}$ equals $V_{F B}, q_{G}=0$, as we know it must (see Fig. 9.3b).

Using Eq. (9.21) to calculate $C_{g s}$, we find that in depletion

$$
\begin{equation*}
C_{g s}\left(V_{\mathrm{FB}}<V_{G S}<V_{T}\right)=\frac{L W C_{\mathrm{ox}}^{*}}{\sqrt{1+\frac{2 C_{\mathrm{ox}}^{*}\left(V_{G S}-V_{\mathrm{FB}}\right)}{\varepsilon_{\mathrm{Si}} q N_{A}}}} \tag{9.27}
\end{equation*}
$$

Looking at this expression, we see that $C_{g s}$ has a value of $C_{o x}^{*} L W$ when $V_{G S}=$ $V_{F B}$ and decreases for $V_{G S}$ greater than the flat-band value. Physically, the depletion region width increases with increasing $v_{G S}$ above $V_{\mathrm{FB}}$. Since the increments in the charge store, $q_{g}$ and $-q_{g}$, are added (and removed) from the gate and the edge of the depletion region, the capacitance of the structure decreases as the effective width of the capacitor (i.e., the separation between $q_{g}$ and $-q_{g}$ ) increases.

Pursuing this line of reasoning further, we can view this structure as two capacitors-the oxide capacitance $L W C_{\mathrm{ox}}^{*}$ and the depletion region capacitance, $L W \varepsilon_{\text {Si }} / x_{D}$-in series. From this viewpoint, we must have

$$
\begin{equation*}
C_{g s}=\frac{L W C_{\mathrm{ox}}^{*} L W\left(\varepsilon_{\mathrm{Si}} / x_{D}\right)}{L W C_{\mathrm{ox}}^{*}+L W\left(\varepsilon_{\mathrm{Si}} / x_{D}\right)} \tag{9.28a}
\end{equation*}
$$

or, simplifying a bit,

$$
\begin{equation*}
C_{g s}=\frac{L W}{\left(x_{D} / \varepsilon_{S \mathrm{i}}\right)+\left(1 / C_{\mathrm{ox}}^{*}\right)} \tag{9.28b}
\end{equation*}
$$

To see that this is equivalent to the expression in Eq. (9.27), we return to Eq. (9.25) for $q_{D}^{*}$ and realize that $x_{D}=q_{D}^{*} / q N_{A}$. Thus we have

$$
\begin{equation*}
\frac{x_{D}}{\varepsilon_{\mathrm{Si}}}=\frac{1}{C_{\mathrm{ox}}^{*}}\left(\sqrt{1+\frac{2 C_{o \mathrm{x}}^{*}}{2} \frac{\left(v_{G S}-V_{\mathrm{FB}}\right)}{\varepsilon_{\mathrm{Si}} q N_{A}}}-1\right) \tag{9.29}
\end{equation*}
$$

When this expression is substituted into Eq. (9.28b), we get Eq. (9.27).

We have said that when $v_{G S}$ reaches $V_{T}$ the depletion region width reaches its maximum and that the additional charge stored for any $v_{G S}$ in excess of $V_{T}$ appears in the inversion layer at the oxide-semiconductor interface. By now you should realize that this means that $C_{g s}$ is just the oxide capacitance $W L C_{o x}^{*}$. To see formally that this is indeed the case, refer to Fig. $9.3 i$; where we see that $q_{G}^{*}$ is now $-q_{N}^{*}+Q_{D T}^{*}$. Using Eq. (9.16) for $q_{N}^{*}$, we have

$$
\begin{equation*}
q_{G}^{*}=W L\left(v_{G S}-V_{T}\right) C_{\mathrm{ox}}^{*}+Q_{D T}^{*} \tag{9.30}
\end{equation*}
$$

and we immediately see that above threshold, $C_{g s}$ is given by

$$
\begin{equation*}
C_{g s}\left(V_{G S}>V_{T}\right)=W L C_{\mathrm{ox}}^{*} \tag{9.31}
\end{equation*}
$$

A convenient way to summarize these results and to appreciate their significance is to plot $C_{g s}$ as a function of $V_{G S}$ over a range of voltages from below the flat-band value to above threshold. An example of such a plot for an MOS capacitor on $p$-type silicon is shown in Fig.9.6a. (The numerical values in this plot correspond to those in the example earlier in this chapter.) As is consistent with our model, we see that for biases below $V_{\mathrm{FB}}$ and above $V_{T}, C_{g s}$ is $W L C_{\mathrm{ox}}^{*}$, which we call simply $C_{0 x}$ in the figure. For a bias between $V_{\mathrm{FB}}$ and $V_{T}$ (i.e., when the structure is in depletion), $C_{g s}$ is less than $C_{o x}$ and decreases nonlinearly with $V_{G S}$.

You can see from Fig. 9.6a that a measurement of $C_{g s}$ versus $V_{G S}$ can yield a great deal of information about an MOS capacitor. First, it provides us with a measurement of $V_{\mathrm{FB}}$ and $V_{T}$. Second, from the value of $C_{g s}$ in the horizontal regions (i.e., from $C_{o x}$ ), we can calculate the oxide thickness $t_{0}$ (assuming we know $\varepsilon_{o}, W$, and $L$ ). Third, from the shape of the plot in depletion we can estimate $N_{A}$. Alternatively, we can also estimate $N_{A}$ from the difference between $V_{T}$ and $V_{F B}$ [see Eq. (9.14)].

In practice, a plot of $C_{g s}$ versus $V_{G S}$ is neither as fiat nor as sharp as our ideal curve in Fig. 9.6a. The problem is that the charge stores in accumulation and inversion are not itteal impulse, or delta, functions at the interface; instead they are distributed over a finite (albeit very thin) layer. Consequently $C_{g s}$ in accumulation and inversion is a bit less than $C_{\text {ox }}$. Furthermore, the threshold does not correspond to a perfectly abrupt change in the state of the surface; rather, it is a specific point along a continuous (albeit sharp) transition, so the change in $C_{g s}$ at $V_{T}$ is not an abrupt step, but rather a more rounded step. Such a "real" $C$ - $V$ plot for an MOS capacitor is plotted as the solid line in Fig. 9.6b; the dashed curve in this figure is the ideal curve from Fig. 9.6a. Modeling and calculating the solid curve in Fig. $9.6 b$ requires the use of the full Poisson-Boltzmann equation, Eq. ( 6.12 b ), just as is necessary if we want to go beyond the depletion approximation model when treating a $p-n$ junction.

Finally, we should consider the effect on $C_{g s}$ of applying a fixed reverse bias $V_{B S}$ between the substrate and the $n^{+}$-regions. (Note that this $V_{B S}$ will be a negative quantity.) Several things happen. First, the flat-band point on the plot is shifted left by $\left|V_{B S}\right|$ because we are now measuring the gate voltage relative to the source, not the substrate. The actual voltage between the gate $G$ and substrate $B$ at flat-band conditions is the same as before, but the corresponding $v_{G S}$ is $\left|V_{B S}\right|$


FIGURE 9.6
Capacitance-voltage ( $C$-V) plots for an MOS capacitor structure like that illustrated in Fig. 9.5 and used in the example earlier in this chapter: (a) $C_{g s}$ versus $V_{G S}$ for $V_{B S}=0$, assuming the depletion model and delta function inversion and accumulation layers; (b) a "real" $C$ - $V$ plot on the same structure, showing the softening of the curve that occurs in practice; (c) $C_{g s}$ versus $V_{G S}$ (depletion model) for the same structure, assuming $V_{B S}=-0.5 \mathrm{~V}$. [The dashed curves in (b) and (c) repeat the ideal, $V_{B S}=0$ curve from (a).]
smaller (i.e., $v_{G S}$ is $v_{G B}+V_{B S}$ and $V_{B S}$ is negative). Second, the threshold point is shifted slightly to the right by an amount $\left[Q_{D T}^{*}\left(V_{B S}\right)-Q_{D T}^{*}(0)\right] / C_{\mathrm{ox}}^{*}$, as you can see by referring to Eq. (9.20), which gives $v_{G B}$ at threshold, the corresponding $v_{G S}$ is $v_{G B}-v S B$, so we obtain

$$
\begin{equation*}
v_{G S}(\text { at threshold conditions })=V_{\mathrm{FB}}+\left|2 \phi_{p}\right|-\frac{t_{o}}{\varepsilon_{o}} Q_{D T}^{*}\left(V_{S B}\right) \tag{9.32}
\end{equation*}
$$

The third change is that value of $C_{g s}$ at this threshold value of $v_{G S}$ is smaller than before because now the threshold depletion region width is larger. These changes are evident in Fig. 9.6c.

### 9.5 IONS AND INTERFACE CHARGES IN MOS STRUCTURES

Before proceeding to summarize our results and then move on to field effect transistors, we must modify our picture slightly to make it more general and to better represent reality. In practice we find that there are often fixed ions (i.e., fixed charges) at the oxide-silicon interface. If wafers become contaminated during processing, it is also possible for there to be ions in the oxide itself. We identify three different types of such nonideal, or extrinsic, charge: interface charge, and fixed and mobile oxide ions.

### 9.5.1 Interface Charge

The charge found at the oxide-silicon interface, which we call interface charge, is usually positive and is the result of a number of causes. A small number of interface charges appears to be intrinsic to (or inherent in) this interface; others arise from imperfections in the fabrication process; still others may be introduced intentionally to adjust certain device characteristics, as we shall see later. In any event, we should allow for the possibility of some fixed charged ions at this interface. We will call this charge $Q_{I}^{*}$, which has units of $\mathrm{C} / \mathrm{cm}^{2}$. Including this fixed interface charge in our plots of potential and net charge through an MOS capacitor in thermal equilibrium modifies these plots as shown in Fig. 9.7. Comparing Figs. $9.7 a$ and $b$ to Fig. 9.2, we see that there is now less potential drop across the oxide and less charge on the left-most electrode in equilibrium, but the depletion region is somewhat wider and the depletion region charge $q N_{A} x_{D}$ has increased.

When we bias the structure to flat-band, we have the situation illustrated in Figs. $9.7 c$ and $d$. There is an additional potential drop $-Q_{I}^{*} t_{0} / \varepsilon_{0}$ across the oxide, and the flat-band voltage is modified to be

$$
\begin{equation*}
V_{\mathrm{FB}}=-\left(\phi_{\mathrm{A} 1}-\phi_{p}\right)-Q_{I}^{*} \frac{t_{0}}{\varepsilon_{0}} \tag{9.33}
\end{equation*}
$$

The convenient thing about $Q_{I}^{*}$ is that it is fixed, so its effects are independent of $v_{G B}$ and can simply be superimposed on all of the effects of our preceding


FIGURE•9.7
Net charge distribution and electrostatic potential profile through an MOS capacitor in thermal equilibrium with a fixed interface charge density $Q_{I}$, under two bias conditions: ( $a$ and $b$ ) $v_{G B}=0$; $(c$ and $d) v_{G B}=V_{F B}$.
discussions. Thus the presence of interface charge will be fully accounted for by using Eq. (9.33) to calculate the flat-band voltage $V_{\mathrm{FB}}$ and by using this value everywhere $V_{\mathrm{FB}}$ appears in our expressions. No other modification is required.

## Example

Question. Suppose the interface sheet charge density $Q_{I}^{*}$ is $10^{11} \mathrm{~cm}^{-2}$, or $1.6 \times$ $10^{-8} \mathrm{C} / \mathrm{cm}^{2}$. In the MOS capacitor that we considered in the preceding example, how much would this interface charge shift the flat-band and threshold voltages?

Discussion. The amount of shift is $-Q_{I}^{*} t_{o} / \varepsilon_{o}$, or in this case approximately -0.12 V . Thus the flat-band voltage would become -0.53 V and the threshold voltage would be reduced to +0.65 V .

Notice in this example that if the interface charge density were another order of magnitude higher, the threshold voltage would become negative and the device would change from enhancement mode (see Sec. 9.6.1) to depletion mode.

### 9.5.2 Oxide Charge

If sufficient care is not taken during processing, it is possible for the oxide in. an MOS structure to be contaminated with ions, usually positively charged ions.

The effect of these ions is very much like that of the interface charge. The only new element is that because they are not all in the same plane, their impact on $V_{F B}$ depends on their distribution within the oxide. Suppose that their charge density profile is given by $\rho_{O}(x)$, in $\mathrm{C} / \mathrm{cm}^{3}$. At flat-band conditions, in addition to this positive oxide charge, there will be a negative charge on the gate electrode equal to the total amount of charge within the oxide. Integrating this charge distribution twice, we find that $V_{\mathrm{FB}}$ will be modified to

$$
\begin{equation*}
V_{\mathrm{FB}}=-\left(\phi_{m}-\phi_{p}\right)-\frac{1}{\varepsilon} \int_{0}^{-t_{0}}\left[\int_{0}^{x} \rho_{O}(x) d x\right] d x \tag{9.34}
\end{equation*}
$$

In general, a distributed oxide charge like this cannot be experimentally distinguished from an interface charge $Q_{I}^{*}$ because both are manifested as a shift in $V_{\mathrm{FB}}$.

Any oxide charge is bad, but the situation is even worse if the ions in the oxide are mobile, which is the case under certain conditions for some common contaminant ions in silicon dioxide (in particular, sodium ions). The problem with such ions is not only that their presence causes a large flat-band and threshold voltage shift, but also that the shift is unstable because the profile $\rho_{O}(x)$ is unstable, so that $V_{\mathrm{FB}}$ and $V_{T}$ wander with time and operating conditions.

The mobility of such ions as sodium can be used to our advantage to develop a diagnostic procedure to measure the total amount of such mobile charge in the following way. Sodium ions, which are the most common oxide contaminant, will move under the influence of an electric field, particularly if the sample is heated to several hundred degrees centigrade. A common measurement technique used to access the quality of an oxide (i.e., to measure the total density of mobile ions) is a voltage stress test. A positive bias is first applied to the gate of an MOS test structure held at high temperature, and the ions are drifted to the oxidesemiconductor interface; the resulting flat-band voltage is measured and labeled $V_{\mathrm{FB}+}$. Then a negative bias is applied so that the ions are drifted to the metal-oxide interface, and the flat-band voltage is measured and called $V_{\mathrm{FB}}-$.

In the first instance, when all of the mobile oxide ions are at the oxidesilicon interface, their contribution to $V_{\mathrm{FB}+}$ is $-Q_{O}^{*} / C_{o x}^{*}$, where $Q_{o}^{*}$ is the total mobile ion sheet concentration in the oxide. In the second case, when all of the ions are at the metal-oxide interface, they make no contribution to $V_{\mathrm{FB}}$. Clearly, we can then calculate $Q_{O}^{*}$ from the difference between $V_{\mathrm{FB}+}$ and $V_{\mathrm{FB}-}$ :

$$
\begin{equation*}
Q_{O}^{*}=\left(V_{\mathrm{FB}-}-V_{\mathrm{FB}+}\right) C_{\mathrm{ox}}^{*} \tag{9.35}
\end{equation*}
$$

The goal in processing is to have $Q_{O}^{*}$ be zero, but when something goes wrong and the oxide becomes contaminated, a voltage stress measurement is a useful way to identify mobile ion contamination and assess the magnitude of the problem.

### 9.6 TYPES OF MOS CAPACITORS

We chose to consider an MOS capacitor made on $p$-type silicon, but we can construct an MOS capacitor on $n$-type silicon just as well. Suitable changes in
sign and polarity have to be made to account for the fact that donors now replace acceptors and the roles of holes and electrons are reversed. When made on $p$-type silicon, MOS structures are referred to as $n$-channel devices, whereas when the bulk of the device is $n$-type, the structures are referred to as $p$-channel devices.

Before ending this chapter, we will collect here the expressions for the key parameters identified in this chapter and state them for devices made on both $n$-type and $p$-type silicon. The expressions of interest are those for the flat-band and threshold voltages, $V_{F B}$ and $V_{T}\left(v_{C B}\right)$, respectively, and for the inversion layer charge density $q_{N}^{*}\left(v_{C B}\right)$.

### 9.6.1 $n$-channel, $p$-type Si

For MOS capacitors fabricated on $p$-type silicon, the flat-band voltage, threshold voltage, and inversion layer charge density are given by Eqs. (9.33), (9.20), and (9.19), respectively. Repeating those equations here, we have, after substituting Eq. (9.18) in Eq. (9.20) and using Eq. (9.20) to simplify Eq. (9.19),

$$
\begin{gather*}
V_{\mathrm{FB}}=-\left(\phi_{m}-\phi_{p}\right)-Q_{I}^{*} \frac{t_{0}}{\varepsilon_{o}}  \tag{9.36}\\
V_{T}\left(v_{C B}\right)=V_{\mathrm{FB}}+\left|2 \phi_{p}\right|+v_{C B}+\frac{t_{0}}{\varepsilon_{o}} \sqrt{2 \varepsilon_{S i} q N_{A}\left(\left|2 \phi_{p}\right|+v_{C B}\right)}  \tag{9.37}\\
q_{N}^{*}\left(v_{C B}\right)= \begin{cases}-\left[v_{G B}-V_{T}\left(v_{C B}\right)\right] \frac{\varepsilon_{0}}{t_{0}} & \text { if } v_{G B} \geq V_{T} \\
0 & \text { if } v_{G B} \leq V_{T}\end{cases} \tag{9.38}
\end{gather*}
$$

We restrict $v_{C B}$ to be greater than zero. $Q_{I}^{*}$ is typically positive.
If the oxide-semiconductor interface is not inverted when $v_{G B}=0$, the threshold voltage will be positive and the inversion layer, or channel, must be created by applying a larger positive gate voltage (i.e., $v_{G B}>V_{T}$ ). This type of device is called an enhancement mode device because an applied gate voltage is required to enhance the channel. If, however, $V_{T}$ is negative, a channel will exist when the gate voltage is zero. This type of device is called a depletion mode device: a gate voltage must be applied to eliminate the channel (i.e., to deplete it of carriers). This latter gate voltage must, of course, be negative.

### 9.6.2 $p$-channel, $n$-type Si

For MOS capacitors fabricated on $n$-type silicon, these expressions change in several ways. $N_{A}$ is replaced by $N_{D}, \phi_{p}$ is replaced by $\phi_{n}$, and $v_{C B}$ must be less than zero. The interface charge $Q_{I}^{*}$ is still typically positive.

The expressions are now

$$
\begin{gather*}
V_{\mathrm{FB}}=-\left(\phi_{m}-\phi_{n}\right)-Q_{I}^{*} \frac{t_{0}}{\varepsilon_{0}}  \tag{9.39}\\
V_{T}\left(v_{C B}\right)=V_{\mathrm{FB}}-2 \phi_{n}+v_{C B}-\frac{t_{0}}{\varepsilon_{0}} \sqrt{2 \varepsilon_{\mathrm{Si}} q N_{D}\left(2 \phi_{n}-v_{C B}\right)} \tag{9.40}
\end{gather*}
$$

$$
q_{P}^{*}\left(v_{C B}\right)= \begin{cases}-\left[v_{G B}-V_{T}\left(v_{C B}\right)\right] \frac{\varepsilon_{o}}{t_{0}} & \text { if } v_{G B} \leq V_{T}  \tag{9.41}\\ 0 & \text { if } v_{G B} \geq V_{T}\end{cases}
$$

Note that now the threshold voltage $V_{T}$ is smaller than the flat-band voltage $V_{F B}$. Also, the gate voltage $v_{G B}$ must be smaller than the threshold voltage for inversion. The entire sequence of states is, in fact, reversed: accumulation occurs when $v_{G B}>v_{F B}$, depletion when $v_{\mathrm{FB}}>v_{G B}>V_{T}$, and inversion when $v_{G B}<V_{T}$.

There are depletion and enhancement mode $p$-channel devices as well. In a $p$-channel structure, however, an enhancement mode device has a negative threshold voltage and a depletion mode device has a positive threshold.

### 9.7 SUMMARY

In this chapter we have introduced our second basic semiconductor device structure, the metal-oxide-semiconductor (MOS) capacitor. We have described three distinct bias conditions of this structure-accumulation, depletion, and inversion-and we have identified the bias voltages defining the boundaries between these regions as the flat-band and threshold voltages, respectively. The fact that we can invert the surface of the semiconductor under the metal electrode in an MOS capacitor structure, inducing an $n$-type layer, or "channel," on a $p$-type substrate and a $p$-type channel on an $n$-type substrate; and that we can control the conductivity of this layer by the voltage that we apply to the metal electrode, is the key to the usefulness of this structure in field effect transistors, as we shall see in Chap. 10.

To quantify our description of the effects of an applied voltage on an MOS capacitor, we have developed the MOS-capacitor equivalent of our depletion approximation model for $p-n$ junctions and have obtained expressions (summarized in Sec. 9.6) for the flat-band and threshold voltages; the depletion region width, charge, and electric field; and the inversion layer charge. We have also incorporated the effects of an interface charge on these parameters and have allowed for the application of a bias to the channel of an MOS capacitor that is biased into inversion.

Finally, we have noted that there are both $n$ - and $p$-channel devices and have developed models (summarized in Sec. 9.6) for both.

## PROBLEMS

9.1 You are given an MOS capacitor made on silicon, and you are told that its flat-band voltage $V_{\mathrm{FB}}$ is +1 V and that its threshold voltage $V_{T}$ is +3 V . You are also told that the thickness $t_{0}$ of the gate insulator is $800 \AA\left(8 \times 10^{-6} \mathrm{~cm}\right)$ with $\varepsilon_{r}=3.9$ ( $\varepsilon_{o} \approx 3.5 \times 10^{-13} \mathrm{~F} / \mathrm{cm}$ ) .
(a) What is the carrier type of the silicon, $n$-type or $p$-type?
(b) What is the condition of the oxidesilicon interface when $\nu_{G B}$ is 0 V ?
(c) For what range of $v_{G B}$ is the silicon surface in what is termed the depletion condition and is neither accumulated nor inverted?
(d) This capacitor is biased such that $\left|v_{G B}-V_{T}\right|=3 \mathrm{~V}$ and the oxide-silicon surface is inverted.
(i) What is the sheet charge density in the inversion layer?
(ii) What is the sheet resistance of this layer? Assume that the electron mobility is $1000 \mathrm{~cm}^{2} / V-s$ and the hole mobility is $500 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}$. Recall that the sheet resistance is defined as side-to-side resistance of a square piece of material and that it has units of ohms per square.
(e) Another MOS capacitor is identical to the first except that its oxide is contaminated with $10^{16} \mathrm{~cm}^{-3}$ sodium ions, $\mathrm{Na}^{+}$.
(i) What is the total charge per $\mathrm{cm}^{2}$ in the oxide?
(ii) Sketch the net charge distribution $\rho(x)$ throughout the structure under flatband conditions. Assume that there is no interface charge $Q_{I}$.
(iii) How much is the flat-band voltage changed by the presence of this charge?
9.2 Consider an MOS capacitor structure like that in Fig. 9.2 but fabricated on an $n$-type Si substrate with $n_{0}=5 \times 10^{16} \mathrm{~cm}^{-3}$ and an oxide thickness of $200 \AA$. Assume zero interface state density initially and an electrostatic potential difference between the gate metal and intrinsic silicon of 0.6 V .
(a) What is the flat-band voltage? (Take the gate to be the positive reference for voltage.)
(b) What is the threshold voltage?
(c) (i) What is the sheet charge density in the inversion layer when the gate voltage is 5 V in excess of the threshold?
(ii) What is the sheet resistance of this charge layer assuming $\mu_{h}=300$ $\mathrm{cm}^{2} / \mathrm{V} \cdot \mathrm{s}$ ?
(d) If there is a positive interface state charge density of $1.6 \times 10^{-9} \mathrm{C} / \mathrm{cm}^{2}$, what will the flat-band and threshold voltages be?
9.3 Consider the MOS capacitor in Fig. 9.5 and assume that $V_{S B}$ is +2 V . Assume also that the other dimensions and doping levels in the structure are the same as those in the example in Sec. 9.2.4.
(a) What is the change in electrostatic potential crossing the depletion region at and above threshold? How does this differ from the value when $V_{S B}$ is zero? (See the example.)
(b) What is the depletion region width at and above threshold?
(c) What is the threshold voltage (i) relative to terminal B and (ii) relative to terminal N?
(d) What is the sheet charge density in the inversion layer when the gate voltage is 2 V in excess of threshold?
(e) What is the flat-band voltage?
9.4 Consider using the MOS structure of problem 9.2 in a device like that pictured in Fig. 9.5 , and assume $v_{B S}$ is zero. The gate electrode area is $0.1 \mathrm{~cm}^{2}$.
(a) Find an expression for the total charge on the gate, $q_{G}$, as a function of $V_{G S}$ for $-5 \mathrm{~V} \leq v_{G S} \leq+5 \mathrm{~V}$. Sketch and label your result.
(b) Find expressions for the gate-to-source capacitance $\partial q_{G} / \partial \nu_{G S}$ as a function of $V_{G S}$ over the same range. Sketch and label your result.
9.5 What would flat-band and threshold voltages be if the MOS structure in the example in Sec. 9.2 .4 had been fabricated on an $n$-type substrate with $N_{D}=2.5 \times 10^{17} \mathrm{~cm}^{-3}$ rather than on a $p$-type substrate?


FIGURE P9.7
9.6 An $n$-channel MOS capacitor with a $600-\AA\left(6 \times 10^{-6} \mathrm{~cm}\right)$ thick gate oxide, $\varepsilon r=4$, becomes contaminated with $10^{10} \mathrm{~cm}^{-2}$ fixed positive ions at the silicon-oxide interface.
(a) By how much does the threshold voltage $V_{T}$ change?
(b) Does $V_{T}$ increase or decrease? Explain your answer physically.
9.7 Assume that there is a uniform density $N$ of positive ions in the oxide of a MOSFET, as illustrated in Fig. P9.7.
(a) Show that the expression for the change in threshold voltage caused by this charge is

$$
\Delta V_{\mathrm{th}}=\frac{1}{\varepsilon_{0}} \int_{0}^{t_{0}}\left[\int_{x}^{x_{0}} \rho(x) d x\right] d x=-\frac{q N t_{o}^{2}}{2 \varepsilon_{0}}
$$

(b) What density $N$ of sodium ions, $\mathrm{Na}^{+}$, will cause a $\Delta V_{\text {th }}=-0.5 \mathrm{~V}$ ? Assume $t_{o}=$ $1000 \AA$. Use $\varepsilon_{r}=3.9$.
(c) If a $0.5-\mathrm{V}$ threshold shift is enough to ruin a certain MOS circuit, how many 3-in.-diameter wafers could a crystal of table salt (a cube 0.1 mm on a side) destroy? Assume that the $\mathrm{Na}^{+}$ions are uniformly distributed throughout a $1000-$


## FIGURE P9.8

$\AA$-thick oxide layer over the entire surface of the wafers. Note: The density of NaCl is $2 \times 10^{22}$ molecules $/ \mathrm{cm}^{3}$.
9.8 The capacitance-voltage relationship measured between the gate and source of a particular MOSFET with $v_{D S}$ and $v_{B S}$ equal to 0 V is shown in Fig. P9.8. The gate of this device measures $20 \mu \mathrm{~m}$ by $100 \mu \mathrm{~m}$.
Use this data to answer the following questions:
(a) What is (i) the threshold voltage $V_{T}$ ? (ii) the flat-band voltage $V_{\mathrm{FB}}$ ?
(b) What is the thickness of the oxide, $t_{0}$ ?
(c) What is the maximum depletion region width $X_{D T}$ ?
(d) (i) What is the carrier type of the substrate, $n$ or $p$ ?
(ii) What is the net doping level of the substrate? Hint: Use Eqs. (9.12) and (9.14) (or their equivalents for an $n$-type substrate) to write $V_{T}-V_{\mathrm{FB}}$ in terms of $X_{D T}$ and the net doping of the substrate. You know $X_{D T}$ from part c, so you can solve for the net doping.
(e) What is the electrostatic potential of the gate metal, $\phi_{m}$, relative to intrinsic silicon?

## CHAPTER 10

## FIELD EFFECT TRANSISTORS

In Chap. 8 we studied the bipolar transistor and saw how the voltage between the base and emitter controlled the current through the device from emitter to collector. One way of visualizing this process is by plotting the potential energy of the majority carriers in the emitter and collector through a bipolar junction transistor; this is done in Fig. 10.1a for an unbiased structure. In Fig. 10.1b the same structure is shown biased in its forward active region. From these plots it is clear that forward-biasing the emitter-base junction in a bipolar junction transistor lowers the potential energy barrier between the emitter and collector presented by the base. When the barrier is reduced, more carriers can surmount it and current flows between the emitter and collector.

In the bipolar junction transistor, direct electrical contact is made to the base. The height of the potential barrier posed by the base is modulated directly by the base-emitter voltage. Another way to control this potential energy barrier is indirectly by means of a field plate; that is, to induce a change in the barrier via a sheet of charge on an adjacent electrode. This approach eliminates the annoyance of having to deal with a control electrode current (i.e., the base current in a bipolar junction transistor), but this advantage comes at the expense of lower transconductance; that is, the control electrode voltage in this approach has less effect on the current than it does when the contact is direct (as it is in a bipolar junction transistor).

Transistors that use a field plate to control current flow are called field effect transistors, or FETs. The control electrode is called the gate rather than the base; the terminal corresponding to the emitter is called the source; and the third terminal is called the drain. There are several types of field effect transistors that are important in modern electronics. We will look at three: the metal-oxidesemiconductor field effect transistor (MOSFET), the junction field effect transistor (JFET), and the metal-semiconductor field effect transistor (MESFET).


FIGURE 10.1
Potential energy of the majority carriers in the emitter of a bipolar junction transistor plotted as a function of position through the device: (a) no bias applied; (b) bias in forward active region,

In addition to the differences in how the barrier to current flow is controlled in BJTs and FETs, there are other important differences that you should watch for as we study FETs in this chapter. First, and by far most important, in an FET the carriers flow between the source and drain by means of drift, whereas the carriers in a BJT flow between the emitter and collector by diffusion. Second, the region between the emitter and collector in a BJT (i.e., the base) is quasineutral. In an FET, the region in which the current flows between the source and drain, which is called the channel, may have a net charge. And finally, an FET will frequently have four terminals, whereas a BJT always has only three.

### 10.1 METAL-OXIDE-SEMICONDUCTOR FIELD EFFECT TRANSISTORS

A metal-oxide-semiconductor field effect transistor, or MOSFET, uses an MOS capacitor structure as its control, or gate. A typical $n$-channel MOSFET structure is illustrated in Fig. 10.2. There are four terminals in this structure; but one, the back gate B , is biased so that negligible current flows through it. We can focus initially on the gate G , source S , and drain D . The basic operating principle is that a voltage is applied between the gate and the source so as to invert the region under the gate electrode to create a conducting channel between the source and drain
regions. Thus, when a voltage is applied between the drain and the source, there will be a current from the drain to the source through this channel. The magnitude of this drain current $i_{D}$ will depend on the drain-to-source voltage $v_{D S}$ and, most importantly, on the gate-to-source voltage $v_{G S}$ (i.e., on the amount of inversion charge in the channel). At low values of $v_{D S}$, the drain current varies linearly with $v_{D S}$, so that the MOSFET looks like a resistor whose value is controlled by $v_{G S}$. As $v_{D S}$ increases, however, the resistive voltage drop along the channel causes the level of inversion to be less at the drain end of the channel than at the source end. The resistance of the channel thus increases as $v_{D S}$ increases, and the drain current increases less rapidly (i.e., sublinearly with $v_{D S}$ ). At high enough drain-to-source voltage the inversion layer disappears completely at the drain end. This point is called pinchoff. Beyond this point, in what is called saturation, the current no longer increases with $v_{D S}$ but stays constant at a level determined by $v_{G S}$ (and, of course, the details of the specific device structure in question). This characteristic is illustrated in Fig. 10.3.

The MOSFET illustrated in Fig. 10.2 is called an $n$-channel MOSFET because the majority carriers in the channel inversion layer are electrons. It is also possible to fabricate $p$-channel MOSFETs in which the inversion layer is comprised of holes. Such a device is made on an $n$-type substrate and has $p$-type source and drain regions.

Our discussion thus far has implied that there is no channel in the absence of a gate-to-source bias (i.e., when $v_{G S}=0$ ). This is indeed the most common situation; we call a device in this situation a normally off, or enhancement mode, MOSFET. In order to turn an enhancement mode MOSFET "on," a channel must be created by applying bias to the gate. It is also possible, however, to fabricate devices in which a channel exists even in the absence of any bias on the gate (i.e., with $v_{G S}=0$ ). This is typically done, for example, by putting a suitable amount of interface charge $Q_{I}^{*}$ under the gate. Such a device is called a normally


FIGURE 10.2
Typical $n$-channel MOSFET structure, which will be used in developing a large-signal model for the terminal characteristic.


FIGURE 10.3
Drain current through a MOSFET as a function of $v_{D S}$ when $v_{G S}$ and $v_{B S}$ are held fixed.
on, or depletion mode, MOSFET. To turn a depletion mode MOSFET "off," a bias must be applied that forces the surface out of inversion and into depletion.

We will now turn to developing a quantitative model describing the MOSFET operation just outlined. We will then develop a small-signal linear model based on our quasistatic large-signal model. Finally, we will extend this small-signal model to high-frequency operation.

### 10.1.1 Large-Signal Model: The Gradual Channel Approximation

To quantify the relationships between the gate, drain, and back contact currents ( $i_{G}, i_{D}$, and $i_{B}$, respectively) and the gate-to-source, drain-to-source, and back-to-source voltages ( $v_{G S}, v_{D S}$, and $v_{B S}$, respectively), we will develop a model called the gradual channel approximation. The MOSFET is intrinsically a twodimensional device with the gate field acting approximately vertically, in what we will take to be the $x$-direction, to induce the channel; and with the drain-to-source voltage acting approximately horizontally, in what we will take to be the $y$-direction, to cause a drift current $i_{D}$ in the channel. In the gradual channel approximation we assume that these two aspects of the problem can be treated as strictly one-dimensional problems. We will first solve the field problem in the $x$ direction to model the inversion layer charge, ignoring the fact that the "vertical" field must have a slight $y$-component. We will then solve the drift problem in the $y$-direction, ignoring the fact that there must be a slight $x$-component to the "horizontal" field in the channel. In most devices these are excellent assumptions and the gradual channel approximation is a very powerful model. The assumptions are so good, in fact, that if we didn't point them out beforehand, you may not even have noticed them, at least on the first time through the model. We will return to further discussion of these assumptions later, after we complete our discussion of large-signal FET models.
a) Basic parabolic model. We will treat an $n$-channel device like that pictured in Fig. 10.2; we begin by restricting our model to certain useful bias ranges.

Specifically we want the drain and source $n^{+}$-regions to always be reverse-biased with respect to the $p$-type silicon region, which we call the substrate, so that the substrate current $i_{B}$ will be negligible. Thus for the device of Fig. 10.2 we insist that $v_{B S} \leq 0$ and $v_{D S} \geq 0$. With this restriction we can immediately conclude that $i_{B} \approx 0$. We can also conclude that another of our currents, the gate current $i_{G}$, is approximately zero as well because the gate is insulated from the substrate by the gate oxide.

To proceed with $i_{D}$ we note that unless the gate-to-source voltage $v_{G S}$ is above threshold there will be no path for conduction between the drain and the source; the drain current will be essentially zero (i.e., $i_{D} \approx 0$ if $v_{G S} \leq V_{T}$ ). Thus we conclude that we need only be concerned with modeling $i_{D}$ when $v_{G S}$ is above threshold and there is an inversion layer to form the channel.

Assume now that the gate-to-source voltage is sufficient to create a channel. Based on our introductory discussions we must anticipate that the channel sheet charge density is a function of position, $q_{N}^{*}(y)$. (Notice that we have taken the $y$-direction as being parallel to the semiconductor-oxide interface and normal to the drain and source, with $y=0$ at the source and $y=L$ at the drain.) Because the source and drain will in general be biased with respect to the $p$-type silicon substrate, the channel is also at some potential $v_{C B}(y)$ relative to the substrate. Clearly this voltage is a function of position $y$ along the channel if $v_{D S} \neq 0$, because at the source end we have $\nu_{C B}(0)=v_{S B}$ and at the drain end we have $v_{C B}(L)=v_{D B}$. If we reference the voltage in the channel to the source, which is the usual convention in modeling FETs, we can write

$$
\begin{gather*}
v_{C S}(0)=0  \tag{10.1}\\
v_{C S}(L)=v_{D S} \tag{10.2}
\end{gather*}
$$

Since the voltage in the channel varies with position, it must have a nonzero gradient, which in turn means that there is an electric field in the channel in the $y$-direction. This field is given by

$$
\begin{equation*}
\mathscr{E}_{y}=-\frac{d v_{C S}}{d y} \tag{10.3}
\end{equation*}
$$

If there is an electric field, there must be drift of the inversion layer carriers (electrons in this case), so there must be an electric current in the channel. This channel charge is the negative of the drain current. This current must be given by the sheet charge density at any point $y, q_{N}^{*}(y)$, times the drift velocity of the charge carriers, $s_{y}$ (which at low and moderate values of electric field is their mobility times the electric field at that point $y$ ), multiplied by the width of the device. Defining $W$ as the device width normal to the $x y$-plane, we thus have

$$
\begin{equation*}
-i_{D}=+W q_{N}^{*}(y) s_{y}(y)=-W q_{N}^{*}(y) \mu_{e} \mathscr{छ}_{y} \tag{10.4a}
\end{equation*}
$$

which, using Eq. (10.3), is

$$
\begin{equation*}
i_{D}=-W \mu_{e} q_{N}^{*}(y) \frac{d v_{C S}}{d y} \tag{10.4b}
\end{equation*}
$$

where $\mu_{e}$ is the drift mobility of the electrons in the channel. Notice that $i_{D}$ itself is not a function of $y$; that is, the current in the channel does not change in going from the drain to the source.

We derived an expression for $q_{N}^{*}$ in terms of $v_{G B}$ and $v_{C B}$ in Chap. 9, Eq. (9.19). Rewriting that expression here, but with the voltages referred to the source rather than to the back, we have

$$
\begin{align*}
q_{N}^{*}\left[v_{C S}(y)\right]= & -\frac{\varepsilon_{o}}{t_{o}}\left[v_{G S}-v_{C S}(y)-\left|2 \phi_{p}\right|-V_{\mathrm{FB}}\right] \\
& +\sqrt{2 \varepsilon_{\mathrm{Si}} q N_{A}\left[\left|2 \phi_{p}\right|+v_{C S}(y)-v_{B S}\right]} \tag{10.5}
\end{align*}
$$

Combining Eqs. (10.4) and (10.5) gives us a single differential equation for $v_{C S}(y)$ :

$$
\begin{equation*}
i_{D}=W \mu_{e} q_{N}^{*}\left[v_{C S}(y)\right] \frac{d v_{C S}(y)}{d y} \tag{10.6}
\end{equation*}
$$

We don't care specifically about $v_{C S}(y)$, however; we are only trying to relate $i_{D}$ to $v_{D S}$, which makes our task easier. If we multiply both sides of Eq. (10.6) by $d y$ and integrate from 0 to $L$ we can get our desired result:

$$
\begin{equation*}
\int_{0}^{L} i_{D} d y=-W \mu_{e} \int_{0}^{L} q_{N}^{*}\left[v_{C S}(y)\right] \frac{d v_{C S}(y)}{d y} d y \tag{10.7}
\end{equation*}
$$

The left-hand integral is simply

$$
\begin{equation*}
\int_{0}^{L} i_{D} d y=i_{D} L \tag{10.8a}
\end{equation*}
$$

The right-hand integral looks complex, but it can easily be changed from an integral performed with respect to position to one done with respect to voltage as follows:

$$
\begin{equation*}
\int_{0}^{L} q_{N}^{*}\left[v_{C S}(y)\right] \frac{d v_{C S}(y)}{d y} d y=\int_{0}^{v_{D S}} q_{N}^{*}\left(v_{C S}\right) d v_{C S} \tag{10.8b}
\end{equation*}
$$

where we have made use of Eqs. (10.1) and (10.2) to get the proper limits on the integral. This integral is now easily performed after substituting Eq. (10.5) for $q_{N}^{*}\left[v_{C S}(y)\right]$. The final result is

$$
\begin{align*}
i_{D}\left(v_{D S}, v_{G S}, v_{B S}\right)= & \frac{W}{L} \mu_{e} \frac{\varepsilon_{o}}{t_{o}}\left\{\left(v_{G S}-\left|2 \phi_{p}\right|-V_{\mathrm{FB}}-\frac{v_{D S}}{2}\right) v_{D S}\right. \\
& +\frac{3}{2} \frac{\dot{t}_{0}}{\varepsilon_{o}} \sqrt{2 \varepsilon_{S i} q N_{A}}\left[\left(\left|2 \phi_{p}\right|+v_{D S}-v_{B S}\right)^{3 / 2}\right. \\
& \left.\left.-\left(2 \phi_{p}-v_{B S}\right)^{3 / 2}\right]\right\} \tag{10.9}
\end{align*}
$$

This result is an expression for the drain current $i_{D}$ in terms of $v_{D S}, v_{G S}$, and $\nu_{B S}$, to be sure, but it is far too complex to be easily used. To get a more useful expression, we should pause and consider the physics of the situation and the
relative sizes of the terms before doing the integration in Eq. 10.8. Specifically we notice that the last term in Eq. (10.5) for $q_{N}^{*}$, which corresponds to the depletion region charge $q_{D}^{*}\left[v_{C S}(y), v_{B S}\right]$, is small and varies slowly with $v_{C S}$. If we assume that it can be approximated by a constant value, usually taken to be $Q_{D}^{*}\left(0, v_{B S}\right)$, the channel charge can then be written as

$$
q_{N}^{*}\left[v_{C S}(y)\right] \approx-\frac{\varepsilon_{o}}{t_{o}}\left[v_{G S}-v_{C S}(y)+\left|2 \phi_{p}\right|-V_{\mathrm{FB}}\right]+Q_{D}^{*}\left(0, v_{B S}\right)
$$

Using this in Eq. (10.8b) we find that our expression for $i_{D}$ is markedly simplified. Instead of Eq. (10.9), we obtain

$$
\begin{equation*}
i_{D}=\frac{W}{L} \mu_{e} \frac{\varepsilon_{o}}{t_{o}}\left[v_{G S}+\left|2 \phi_{p}\right|-V_{\mathrm{FB}}+\frac{t_{o}}{\varepsilon_{o}} Q_{D}^{*}\left(0, v_{B S}\right)-\frac{v_{D S}}{2}\right] v_{D S} \tag{10.10a}
\end{equation*}
$$

This expression is much easier to work with than Eq. (10.9), and yet it has a remarkably similar shape because the assumption we made concerning $Q_{D}^{*}$ is a very good one. In the field, making this assumption is known as "ignoring the body effect."

We will usually write Eq. (10.10a) as

$$
\begin{equation*}
i_{D}\left(v_{D S}, v_{G S}, v_{B S}\right)=K\left[v_{G S}-V_{T S}-\frac{v_{D S}}{2}\right] v_{D S} \tag{10.10b}
\end{equation*}
$$

where $K$ is defined as

$$
\begin{equation*}
K \equiv \frac{W}{L} \mu_{e} \frac{\varepsilon_{0}}{t_{0}} \tag{10.11}
\end{equation*}
$$

and $V_{T S}$ is the threshold voltage relative to the source, defined as

$$
\begin{equation*}
V_{T S}\left(v_{B S}\right) \equiv V_{\mathrm{FB}}-\left|2 \phi_{p}\right|-\frac{t_{o}}{\varepsilon_{o}} Q_{D}^{*}\left(0, v_{B S}\right) \tag{10.12a}
\end{equation*}
$$

We write the dependence on $v_{B S}$ explicitly to remind ourselves that $V_{T}$ is a function of $v_{B S}$ through $Q_{D}^{*}$ :

$$
\begin{equation*}
Q_{D}^{*}\left(0, v_{B S}\right)=-\sqrt{2 \varepsilon_{S \mathrm{~S}} q N_{A}\left(\left|2 \phi_{p}\right|-v_{B S}\right)} \tag{10.13}
\end{equation*}
$$

Combining Eq. (10.13) with (10.12a) yields

$$
\begin{equation*}
V_{T S}\left(v_{B S}\right)=V_{\mathrm{FB}}-\left|2 \phi_{p}\right|+\frac{t_{0}}{\varepsilon_{o}} \sqrt{2 \varepsilon_{S i} q N_{A}\left(\left|2 \phi_{p}\right|-v_{B S}\right)} \tag{10.12b}
\end{equation*}
$$

which is a common way of writing $V_{T S}\left(v_{B S}\right)$. Another common way of writing the threshold voltage is in terms of its value for $v_{B S}=0$. A little algebra will show you that we can write

$$
\begin{equation*}
V_{T S}\left(v_{B S}\right)=V_{T S}(0)+\gamma\left[\sqrt{\left(\left|2 \phi_{p}\right|-v_{B S}\right)}-\sqrt{\left|2 \phi_{p}\right|}\right] \tag{10.12c}
\end{equation*}
$$



FIGURE 10.4
Equation (10.10b) plotted (solid lines) for four values of gate-to-source voltage $v_{G S}$ greater than the threshold voltage $V_{T}$ for a fixed value of back-to-source voltage $v_{B S}$.
where $\gamma$, which is called the body effect coefficient, is defined as

$$
\begin{equation*}
\gamma \equiv \frac{t_{o}}{\varepsilon_{0}} \sqrt{2 \varepsilon_{S_{1}} q N_{A}} \tag{10.14}
\end{equation*}
$$

If we plot Eq. (10.10b) for $i_{D}$ as a function of $v_{D S}$ for fixed values of $v_{G S}$ and $\nu_{B S}$, we find that we get inverted parabolas, as illustrated for four values of $v_{G S}$ in Fig. 10.4. In a real device, however, we find that the current does not decrease after reaching its peak; instead, it stays constant at its peak value, as indicated by the horizontal lines in Fig. 10.5. What is going on? The answer is that as $v_{D S}$ increases, the inversion layer charge decreases at the drain end of the channel. It drops all the way to zero when the voltage from the gate to the


FIGURE 10.5
Characteristics for an $n$-channel MOSFET as described by Eq. (10.15) drawn for four values of gate-to-source voltage $v_{G S}$ above threshold and for $v_{B S} \leq 0$.
drain, $v_{G D}$, decreases to the threshold voltage $V_{T}$. This occurs at a drain-to-source voltage of $v_{G S}-V_{T}$, which is precisely the value of $v_{D S}$ at which $i_{D}$ reaches its peak value, $K\left(v_{G S}-V_{T}\right)^{2} / 2$. For larger $v_{D S}$ the current does not decrease, because that would imply less voltage drop in the channel from source to drain. Instead the current stays constant at its peak value; that is,

$$
i_{D}=\frac{K}{2}\left(v_{G S}-V_{T}\right)^{2} \quad \text { when } v_{D S} \geq V_{G S}-V_{T}
$$

The excess of $v_{D S}$ over $v_{G S}-V_{T}$ appears as an ohmic voltage drop across the now very high-resistance short section of channel near the drain.

This completes our large-signal gradual channel approximation model for the MOSFET. In summary, when $v_{B S} \leq 0$ and $v_{D S} \geq 0$ the gate and substrate currents, $i_{G}$ and $i_{B}$, respectively, are zero and the drain current is described by one of three expressions:

$$
i_{D}= \begin{cases}0 & \text { for }\left(v_{G S}-v_{T}\right) \leq 0 \leq v_{D S}  \tag{10.15a}\\ \frac{K}{2}\left(v_{G S}-V_{T}\right)^{2} & \text { for } 0 \leq\left(v_{G S}-V_{T}\right) \leq v_{D S} \\ K\left(v_{G S}-v_{T}-\frac{v_{D S}}{2}\right) v_{D S} & \text { for } 0 \leq v_{D S} \leq\left(v_{G S}-v_{T}\right)\end{cases}
$$

The output characteristic (i.e., $i_{D}$ versus $v_{D S}$ for various values of $v_{G S}$ ) is presented in Fig. 10.5. The three regions in this characteristic corresponding to the three expressions for $i_{D}$ in Eqs. (10.15) are called the cutoff, saturation, and linear (or triode) regions, respectively. Notice that the saturation region in a MOSFET is much different than saturation in a bipolar transistor. Also, the parameter defining the family of curves is a voltage, $v_{G S}$, rather than a current (as in a BJT), and the curves are not evenly spaced for equal increments of $v_{G S}$ (as they were for equal increments of $i_{B}$ in a BJT).

## Example

Question. Consider an $n$-channel MOSFET that incorporates in the gate the MOS capacitor structure in the examples in Chap. 9. The channel length $L$ is $1 \mu \mathrm{~m}$, and the channel width $W$ is $20 \mu \mathrm{~m}$. The electron mobility in the channel is $750 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}$; What is the value of $K$ for this device, and what will the drain current $i_{D}$ be in saturation when the gate-to-source voltage $v_{G S}$ is 2 V ? Recall that $V_{T}$ for this structure is 0.65 V .

Discussion. Using the expression for $K$, that is, $(W / L) \mu_{e}\left(\varepsilon_{0} / t_{o}\right)$, we calculate that $K$ is approximately $1.0 \mathrm{~mA} / \mathrm{V}^{2}$. Thus we find that when $v_{G S}$ is $2 \mathrm{~V},\left(v_{G S}-V_{T}\right)$ is 1.35 V . From Eq. (10.15b), the drain current in saturation is approximately 0.9 mA .

The magnitude of the drain current, about 1 mA , is a typical bias level that we often encounter in bipolar transistors. You will notice, however, that to achieve this current level with our MOSFET we had to apply substantially more input bias voltage than is needed with a BJT (i.e., 2 V versus roughly 0.6 V ). This is in spite of the fact that this MOSFET is actually somewhat larger than a typical bipolar
transistor. This is a common result, and in general FETs tend to be lower-current devices than BJTs.

You may have noticed that the mobility specified in this question is about half the value that we have been assuming for electrons in our previous discussions. The reason is that the electrons in the channel undergo more scattering than those in the "bulk" because of the strong normal electric field from the gate and because they are confined so closely to the semiconductor-oxide interface.

The characteristics described by Eqs. (10.15) and illustrated in Fig. 10.5 correspond to an $n$-channel MOSFET and hold for both enhancement and depletion mode devices. The only difference is that the threshold voltage is greater than zero for an enhancement mode $n$-channel MOSFET, whereas it is less than zero for a depletion mode $n$-channel MOSFET. This is illustrated in Figs. $10.6 a$ and $b$, which show the output characteristics of an enhancement and a depletion mode $n$-channel MOSFET, respectively.

For $p$-channel MOSFETs, all of the voltages and currents change sign, but otherwise the characteristics are identical. The gate current $i_{G}$ is, of course, zero, and we must now have $v_{B S} \geq 0$ and $v_{D S} \leq 0$ to ensure that $i_{B}=0$. The expressions for the drain current $i_{D}$ are

$$
i_{D}= \begin{cases}0 & \text { for } v_{D S} \leq 0 \leq\left(v_{G S}-V_{T}\right)  \tag{10.16a}\\ -\frac{K}{2}\left(v_{G S}-V_{T}\right)^{2} & \text { for } v_{D S} \leq\left(v_{G S}-V_{T}\right) \leq 0 \\ -K\left(v_{G S}-V_{T}-\frac{v_{D S}}{2}\right) v_{D S} & \text { for }\left(v_{G S}-V_{T}\right) \leq v_{D S} \leq 0\end{cases}
$$

where $K$ is $(W / L) \mu_{h}\left(\varepsilon_{o} / t_{o}\right) . V_{T}$ is negative for an enhancement mode $p$-channel device and positive for a depletion mode $p$-channel device. The characteristics of enhancement mode and depletion mode p-channel MOSFETs are illustrated in Figs. $10.6 c$ and $d$. For the sake of illustration, the threshold voltage in this figure has been taken to be either plus or minus two volts. The threshold voltage can, of course, have any magnitude.

The circuit symbols used for the various types of MOSFETs are also illustrated in Fig. 10.6. Notice that the arrow indicates the direction of forward current flow through the substrate-to-channel diodes and that the heavy solid line symbolizes the existence of a channel with zero gate bias in the depletion mode devices. Alternatively, some people draw the arrow on the source terminal in such a way as to indicate the normal direction of current flow; others indicate enhancement mode devices with a broken line between drain and source (solid for depletion mode).

With the bipolar junction transistor and the Ebers-Moll model it was possible to find a very convenient circuit representation for the terminal characteristics using ideal exponential diodes and dependent current sources. To do something similar for the MOSFET, we would have to use a single dependent current source whose value depends on the voltages on the various terminals according to Eqs. (10.15) or Eqs. (10.16), as illustrated for an $n$-channel device in Fig. 10.7. Such a model is much less satisfying than the Ebers-Moll circuit, however, because

(a)


(c)

(b)

(d)

FIGURE 10.6
Output characteristics for the four types of MOSFETs: (a) $n$-channel enhancement mode, $V_{T}=2 \mathrm{~V}$; (b) n-channel depletion mode, $V_{T}=-2 \mathrm{~V}$; (c) $p$-channel enhancement mode, $V_{T}=-2 \mathrm{~V}$; (d) $p$-channel depletion mode, $V_{T}=2 \mathrm{~V}$. The corresponding circuit symbols are also shown.
little additional insight is gained by using it and it does not appreciably simplify the calculation of large-signal voltages and currents. In most solutions, Eqs. (10.15) or Eqs. (10.16) are used directly.
b) More advanced modeling. The basic parabolic MOSFET model is extremely useful and easy to use for hand calculations. However, when it is necessary or


FIGURE 10.7
Circuit representation of the large-signal model for a
MOSFET as described by the gradual channel approximation, Eq. (10.15). Use of this model is
restricted to $v_{B S} \leq 0$ and $v_{D S} \geq 0$.
desirable to include effects not treated in the basic model, certain additions are commonly made to the basic model. We want to look at several common "fixes" now. The models we will develop should be viewed as more advanced in much the same way as the Gummel-Poon BJT model is more advanced than the EbersMoll model. We will not use these models in most of what we do, but it is worth your while to be aware of their existence and origin.

The first effect we will add to our basic model is channel length modulation, or the MOSFET equivalent of the Early effect in BJTs. In saturation, the effective length of the channel decreases with increasing $v_{D S}$ because the width of the region near the drain where the channel has disappeared increases slightly as $v_{D S}$ increases above its value at saturation, $v_{G S}-V_{T}$. This means that the $K$-factor, $(w / L) \mu_{e}\left(\varepsilon_{o} / t_{o}\right)$, increases with increasing $v_{D S}$ and thus that the drain current does not truly saturate at a fixed value; instead, it increases slightly with increasing $v_{D S}$. A common way to model this effect is to assume that in saturation the effective channel length $L_{\text {eff }}$ is given by

$$
\begin{equation*}
L_{\mathrm{eff}} \approx \frac{L}{1+\left[\left(V_{D S}-V_{D S \mathrm{sat}}\right) /\left|V_{A}\right|\right]} \tag{10.17}
\end{equation*}
$$

where $V_{A}$ is called the Early voltage, and $V_{D s_{s \mathrm{sa}}}$ is the voltage at which the device goes into saturation. (We will discuss $V_{D S_{s a t}}$ at more length below.)* Our earlier expression for $i_{D}$ is unchanged in the linear region of operation, but in saturation

[^5]we replace $L$ with $L_{\text {eff }}$. For example, our model for an $n$-channel MOSFET would become
\[

i_{D}=\left\{$$
\begin{array}{lr}
0 & \text { for }\left(v_{G S}-V_{T}\right) \leq 0 \leq v_{D S}  \tag{10.18a}\\
\frac{K}{2}\left(v_{G S}-V_{T}\right)^{2}\left[1+\frac{\left.v_{D S}-V_{D S_{s a t}}-\frac{\left(v_{G S}-V_{T}\right)^{2}}{4\left|V_{\mathrm{A}}\right|^{2}}\right]}{} \begin{array}{ll} 
& \text { for } 0 \leq\left(v_{G S}-V_{T}\right), \\
& v_{D S_{s a t} \leq v_{D S}} \\
K\left(v_{G S}-V_{T}-\frac{v_{D S}}{2}\right) v_{D S} & \text { for } 0 \leq\left(v_{G S}-V_{T}\right), \\
v_{D S} \leq v_{D S_{s 41}}
\end{array}\right.
\end{array}
$$\right.
\]

with $v_{D S_{s a 1}}$ defined as $\left(v_{G S}-V_{T}\right)-\left(v_{G S}-V_{T}\right)^{2} / 2\left|V_{A}\right|$. Only the expression for the drain current in saturation, Eq. 10.18b, has changed. Looking at it, you will recognize that it is our earlier expression multiplied by a factor (the term in square brackets). The bulk of this factor comes directly from substituting Eq. (10.17) in for $L$, but a small correction term is needed to make the curves continuous in going from the linear region into saturation. Eqs. (10.18) are plotted as solid curves in Fig. $10.8 a$ for several values of $v_{G S}-V_{T}$, for a device in which $K$ is $1.0 \mathrm{~mA} / \mathrm{V}^{2}, V_{T}$ is 0.6 V , and $V_{A}$ is -20 V . For comparison, the dashed curves show the characteristics for the same device assuming no channel length modulation, i.e., $\left|V_{A}\right|=\infty$.

At this point it is useful to spend a few lines discussing how $v_{D S_{s u t}}$ is determined. When there is no channel length modulation, $v_{D S_{s t}}$ is $v_{G S}-v_{T}$, which is the value of $v_{D S}$ that corresponds to the peak of the parabolic expression for $i_{D}$ in the linear region (see Fig. 10.4). Notice that this is also the value of $v_{D S}$ at which $d i_{D} / d v_{D S}$ is zero. Thus it is the value of $v_{D S}$ where the incremental channel conductance becomes zero, which is its value in saturation when there is no channel length modulation. We use this observation to extend the concept of saturation to the case where channel length modulation is an issue. In particular, we say that saturation occurs when $d i_{D} / d v_{D S}$, calculated using the expression for $i_{D}$ in the linear region, equals the output condunctance in the saturation region. A bit of algebra shows that this occurs when $V_{D S}$ equals $v_{D S s u}$ as defined above following Eq. 10.18 .

There are a number of variants of Eqs. (10.18a) through (10.18c) that you may see used to treat channel length modulation in MOSFETs, and it is perhaps useful to say a few words about some of them now. A common approach is to approximate $L_{\text {eff }}$ as

$$
L_{\mathrm{eff}} \approx \frac{L}{1+\frac{V_{D S}}{\left|V_{A}\right|}}
$$

That is, $v_{D S_{s u}}$ is left out of the expression. Then this value is substituted for $L$ in the expression for the drain current in the saturation region (just as we did before) and in the expression for the current in the linear region (this must be done so that $i_{D}$ will be continuous when going from one region to the other). Our original definition of the boundary between the linear and saturation regions is retained

(a)

(b)

FIGURE 10.8
The output characteristics for an $n$-channel MOSFET showing the effect of channel length modulation. The solid curves are calculated using Eqs. ( 10.18 ) assuming a $K$-factor of $1.0 \mathrm{~mA} / \mathrm{V}^{2}$, a threshold voltage of 0.6 V , and an Early voltage of -20 V ; the dashed curves were calculated assuming no channel length modulation, i.e., using Eqs. (10.15) or, equivalently, assuming $\left|V_{A}\right|=\infty$ in Eqs. (10.18). (b) The output characteristics for an $n$-channel MOSFET showing the impact of a body effect. The solid curves are calculated using Eqs. (10.18) assuming a $K$-factor of $0.7 \mathrm{~mA} / \mathrm{V}^{2}$, a threshold voltage of 0.6 V , an $\alpha$ of 0.3 , and no channel length modulation. The dashed curves were calculated assuming a $K$-factor of $1.0 \mathrm{~mA} / \mathrm{V}^{2}$ and no body effect, i.e., using Eqs. (10.15) or, equivalently, assuming $\alpha=0$ in Eqs (10.25).
(i.e., it is defined as when $v_{D S}=v_{G S}-V_{T}$ ), and the device characteristics become

$$
i_{D}=\left\{\begin{array}{lr}
0 & \left(v_{G S}-V_{T}\right) \leq 0  \tag{10.18d}\\
\frac{K}{2}\left(v_{G S}-V_{T}\right)^{2}\left[1+\frac{v_{D S}}{\left|V_{A}\right|}\right] & 0 \leq\left(v_{G S}-V_{T}\right) \leq v_{D S} \\
K\left(v_{G S}-v_{T}-\frac{v_{D S}}{2}\right) v_{D S}\left[1+\frac{v_{D S}}{\left|V_{A}\right|}\right] & 0 \leq v_{D S} \leq\left(v_{G S}-V_{T}\right)
\end{array}\right.
$$

Looking at these expressions and comparing them to our earlier equations, we see that we are simply ignoring higher order terms, and that by doing so we end up with expressions that are much more familiar to us, that look less formidable, and that are in general easier to work with. It is common to see that these expressions have been further simplified by leaving the term involving $\left|V_{A}\right|$ out of the expression for the linear region. (In effect, $L_{\text {eff }}$ is substituted for $L$ only in the expression for the saturation region, just as we did originally.) When this is done, both the characteristic and its slope are discontinuous in going from the linear region to the saturation region (as opposed to just the slope being discontinuous, as is the case when the expression for $L_{\text {eff }}$ given by Eq. $10.17^{\prime}$ is substituted for $L$ in the expressions for both regions). Nonetheless, the channel length modulation effect is really important only in saturation, so this makes some sense. Furthermore, such modest discontinuities are not troublesome when doing hand calculations; they are much more troublesome to computers, but computers can handle the more complex expressions, and there is no need to simplify things for them.

Another effect often dealt with differently when extending the basic model is the body effect. In deriving the basic parabolic model we said that the depletion region charge under the gate was approximately constant from one end of the channel to the other and that the channel charge $q_{N}^{*}$ could be approximated using Eq. (10.5'). The body effect is then felt only in its effect on the threshold voltage, $V_{T}$. Another common approximation is to model $q_{N}^{*}$ differently. Returning to Eq. (10.5), we do not neglect $v_{C S}(y)$ under the square root in the last term; instead, we expand the square root dependence. First, we write the last term as follows:

$$
\begin{equation*}
\sqrt{2 \varepsilon_{S i} q N_{A}\left[\left|2 \phi_{p}\right|+v_{C S}(y)-v_{B S}\right]}=\sqrt{2 \varepsilon_{S i} q N_{A}\left[\left|2 \phi_{p}\right|-v_{B S}\right]} \sqrt{1+\frac{v_{C S}(y)}{\left|2 \phi_{p}\right|-v_{B S}}} \tag{10.19}
\end{equation*}
$$

Focusing on the last term on the right-hand side of this equation we make the following approximation:

$$
\begin{equation*}
\sqrt{1+\frac{v_{C S}(y)}{\left|2 \phi_{p}\right|-v_{B S}}} \approx 1+\frac{v_{C S}(y)}{2\left(\left|2 \phi_{p}\right|-v_{B S}\right)} \tag{10.20}
\end{equation*}
$$

This approximation is, strictly speaking, valid only if $v_{C S}$ is much less than $2\left(\left|2 \phi_{p}\right|-v_{B S}\right)$; this will not always be true, but we make the approximation anyway.

With this approximation, we can write $q_{N}^{*}$ as

$$
\begin{align*}
q_{N}^{*}\left[v_{C S}(y)\right] \approx & -\frac{\varepsilon_{o}}{t_{o}}\left\{v_{G S}-v_{C S}(y)-\left|2 \phi_{p}\right|-V_{\mathrm{FB}}\right. \\
& \left.-\frac{t_{0}}{\varepsilon_{o}} \sqrt{2 \varepsilon_{S i} q N_{A}\left(\left|2 \phi_{p}\right|-v_{B S}\right)}\left[1+\frac{v_{C S}(y)}{2\left(\left|2 \phi_{p}\right|-v_{B S}\right)}\right]\right\} \tag{10.21a}
\end{align*}
$$

which becomes, after a bit of algebra,

$$
\begin{align*}
q_{N}^{*}\left[v_{C S}(y)\right] \approx & -\frac{\varepsilon_{o}}{t_{o}}\left\{v_{G S}-\left|2 \phi_{p}\right|-V_{\mathrm{FB}}-\frac{t_{o}}{\varepsilon_{o}} \sqrt{\left(2 \varepsilon_{\mathrm{Si}} q N_{A}\left(\left|2 \phi_{p}\right|-v_{B S}\right)\right.}\right. \\
& \left.-v_{C S}(y)\left[1+\frac{t_{o}}{\varepsilon_{o}} \sqrt{\frac{\varepsilon_{S i} q N_{A}}{2\left(\left|2 \phi_{P}\right|-v_{B S}\right)}}\right]\right\} \tag{10.21b}
\end{align*}
$$

We now define the threshold voltage just as we did earlier:

$$
\begin{equation*}
V_{T S}\left(v_{B S}\right) \equiv V_{\mathrm{FB}}+\left|2 \phi_{p}\right|+\frac{t_{o}}{\varepsilon_{o}} \sqrt{2 \varepsilon_{S i} q N_{A}\left(\left|2 \phi_{p}\right|-v_{B S}\right)} \tag{10.22}
\end{equation*}
$$

which is identical to Eq. (10.12b). We also define a factor $\alpha$ as

$$
\begin{equation*}
\alpha \equiv 1+\frac{t_{0}}{\varepsilon_{0}} \sqrt{\frac{\varepsilon_{S i} q N_{A}}{2\left[2 \phi_{p-S i} \mid-v_{B S}\right]}} \tag{10.23}
\end{equation*}
$$

Using these definitions, we can write

$$
\begin{equation*}
q_{N}^{*}\left[v_{C S}(y)\right] \approx-\frac{\varepsilon_{o}}{t_{o}}\left[v_{G S}-V_{T}-\alpha v_{C S}(y)\right] \tag{10.24}
\end{equation*}
$$

Putting this into Eq. (10.7) and doing the integration yields the following model:

$$
i_{D}=\left\{\begin{array}{lr}
0 & \text { for } \quad\left(v_{G S}-V_{T}\right) / \alpha \leq 0 \leq v_{D S} \\
\frac{K}{2 \alpha}\left(v_{G S}-V_{T}\right)^{2}\left[1+\frac{v_{D S}-V_{D S_{s a t}}}{\left|V_{\mathrm{A}}\right|}-\frac{\left(v_{G S}-V_{T}\right)^{2}}{4 \alpha^{2}\left|V_{A}\right|^{2}}\right]  \tag{10.25b}\\
K\left(v_{G S}-V_{T}-\frac{\alpha v_{D S}}{2}\right) v_{D S} & \text { for } 0 \leq\left(v_{G S}-V_{T}\right), \\
\quad V_{D S_{s a t}} \leq v_{D S}
\end{array}\right.
$$

with $V_{D S S a t}$ now defined as $\left(v_{G S}-V_{T}\right) / \alpha-\left(v_{G S}-V_{T}\right)^{2} /\left(2 \alpha^{2} / V_{A}\right)$. These current expressions are very similar to our earlier results, Eqs. (10.15) and (10.18), but in this model saturation occurs at a somewhat higher voltage and somewhat higher current level than in our basic parabolic model. Figure $10.8 b$ compares the predictions of this model with the basic parabolic model, without the Early effect (i.e., $\left|V_{A}\right|=\infty$, assuming a threshold voltage of 0.6 V , an $\alpha$ of 1.3 , and a $K$-factor of
$0.7 \mathrm{~mA} / \mathrm{V}^{2}$. This $\alpha$ corresponds to a structure similar to the one that we analyzed earlier (see page 273). For comparison, the dashed curves show the characteristics when the body effect is negligible, i.e., when $\alpha \approx 1$. In calculating the dashed curves we take $K$ to be $1.0 \mathrm{~mA} / \mathrm{V}^{2}$ so that both sets of characteristics saturate at the same current level. This makes the increase in saturation voltage due to the body effect more evident. It also corresponds to the situation we typically find in practice. That is to say, we are often comparing how well several different models fit measured data on a given device, and in such a case the meaningful thing to do is to adjust the $K$-factor in the models we are comparing to give the same saturation currents, as was done in Fig. 10.8b.

A common situation is one in which we are trying to fit data measured on a particular device. In such a case the meaningful thing to do is adjust the $K$ factor in our models to predict the same saturation currents. This is done in Fig. $10.8 b$. The curves calculated using the basic model, Eqs. (10.18), are calculated assuming that $K$ is $1.0 \mathrm{~mA} / \mathrm{V}^{2}$ (as before), and the curves calculated using Eqs. (10.25) assume a $K$-factor of $1.4 \mathrm{~mA} / \mathrm{V}^{2}$.
$\alpha$ approaches one with increasing substrate reverse bias. This is true because physically $\alpha$ is the ratio of the depletion region capacitance (with $v_{D S}=0$ ) to the total gate capacitance (oxide and depletion region capacitances in series).

We often approximate $\alpha$ as one for simplicity in hand calculations.
The final additions that we can make to our basic model, which are also included in SPICE, are to add resistors in series with the gate, source, and drain (these are typically very small-value resistors); to add exponential diodes between the source and the substrate and between the drain and the substrate to represent the source-to-substrate and drain-to-substrate diode junctions, respec-tively; and to add a high-value resistor in parallel with the channel between the source and drain to represent any possible source-to-drain leakage path in parallel with the channel. A circuit schematic including all of these elements is presented in Fig. 10.9 .
c) Velocity Saturation in Silicon MOSFETs. We mentioned in Sec. 3.1.1, and saw in Fig. 3.2, that the velocity/electric-field relationship for holes and electrons in silicon is linear at low fields (from which we define the mobility $\mu$ as $s / 8$ ), but at high fields the velocity no longer increases with increasing electric field. Thus we say that the velocity saturates.

In modern, short-channel MOSFETs it is possible that the channel electric field $\mathscr{E}_{y}$ can be high enough to result in velocity saturation. In such a case our replacement of $s_{y}$ with $\mu_{e} \mathscr{E}_{y}$ in Eq. (10.4) is wrong and the current-voltage expressions we developed are similarly incorrect. Although this is not the case for most silicon MOSFETs, it may be true for so-called submicron MOSFETs (i.e., devices with gate lengths less than $1 \mu \mathrm{~m}$ ). To model these devices we should use a different expression to relate $s_{y}$ to $\mathscr{E}_{y}$. A commonly used model, especially in materials like silicon in which the saturation of $s_{y}$ is rather gradual, is

$$
\begin{equation*}
s_{y}\left(\mathscr{E}_{y}\right)=\frac{\mu_{e} \mathscr{E}_{y}}{1+\left(\mathscr{E}_{y} / \mathscr{E}_{\text {crit }}\right)} \tag{10.26}
\end{equation*}
$$



FIGURE 10.9
Circuit schematic representation of a model for an $n$-channel MOSFET including lead series resistances, the source-to-substrate and drain-to-substrate diodes, and a resistor representing source-to-drain leakage. The user must decide whether to represent the dependent current generator using Eqs. (10.15), (10.18), or (10.25).
where $\mu_{e}$ is the traditional low field mobility and $\mathscr{E}_{\text {crit }}$ is the field at which $s_{y}$ is half its saturation value.* For the data in Fig. 3.2, $\mathscr{E}_{\text {crit }}$ is $5 \times 10^{3} \mathrm{~V} / \mathrm{cm}$ and $\mu_{e}$ is $1300 \mathrm{~cm}^{2} / V \cdot \mathrm{~s}$. In a Si MOSFET channel the mobility is lower because the carriers are moving near the oxide-silicon interface; typical values are 200 to 300 $\mathrm{cm}^{2} / \mathrm{V} \cdot \mathrm{s}$ for $\mu_{e}$, and $5 \times 10^{4} \mathrm{~V} / \mathrm{cm}$ for $\mathscr{E}_{\text {crit }}$.

If we use Eq. (10.26) in Eq. (10.4) we find

$$
\begin{equation*}
i_{D}=W q_{N}^{*} \frac{\mu_{e} \mathscr{E}_{y}}{1+\left(\mathscr{E}_{y} / \mathscr{E}_{\text {crit }}\right)} \tag{10.27}
\end{equation*}
$$

Since we know that we are going to want to substitute $-d v_{c s} / d y$ for $\mathscr{E}_{y}$ and integrate, it is best to rearrange this equation a bit. Multiplying both sides by $\left(1+\mathscr{E}_{y} / \mathscr{E}_{\text {crit }}\right)$ and collecting terms involving $\mathscr{E}_{y}$ on the left, we have

$$
\begin{equation*}
i_{D}=\left(W q_{N}^{*} \mu_{e}-\frac{i_{D}}{\mathscr{E}_{\text {crit }}}\right) \mathscr{E}_{y} \tag{10.28}
\end{equation*}
$$

[^6]If we now make our substitution for $\mathscr{C}_{y}$ and use Eq. (10.5') for $q_{N}^{*}$ and Eq. (10.12a) for $V_{T}$, we have

$$
\begin{equation*}
i_{D} d y=\left[W \mu_{e} \frac{\varepsilon_{o}}{t_{o}}\left(v_{G S}-v_{C S}-V_{T}\right)-\frac{i_{D}}{\mathscr{E}_{\text {crit }}}\right] d v_{C S} \tag{10.29}
\end{equation*}
$$

Integrating from one end of the channel to the other we have

$$
\begin{equation*}
i_{D} L=W \mu_{e} C_{\mathrm{ox}}^{*}\left[\left(v_{G S}-V_{T}\right) v_{D S}-\frac{v_{D S}^{2}}{2}\right]-\frac{i_{D} v_{D S}}{\mathscr{C}_{\mathrm{crit}}} \tag{10.30}
\end{equation*}
$$

where we have also written $\varepsilon_{o} / t_{o}$ as $C_{o x}^{*}$. Solving for $i_{D}$ yields

$$
\begin{equation*}
i_{D}=\frac{W}{L+\left(v_{D S} / \mathscr{E}_{\mathrm{crit}}\right)} \mu_{e} C_{\mathrm{ox}}^{*}\left(v_{G S}-V_{T}-\frac{v_{D S}}{2}\right) v_{D S} \tag{10.31a}
\end{equation*}
$$

which can also be written as

$$
\begin{equation*}
i_{D}=\frac{1}{1+\left(v_{D S} / L \mathscr{E}_{\text {crit }}\right)} K\left(v_{G S}-V_{T}-\frac{v_{D S}}{2}\right) v_{D S} \tag{10.31b}
\end{equation*}
$$

where $K$ is $\mu_{e} C_{o x}^{*} W / L$ as before [see Eq. (10.11)]. This is the same as our earlier result except for the leading term. Again it is valid until $i_{D}$ reaches its peak at some value of $v_{D S}$ that we call $v_{D S, \text { sat }}$, at which point $i_{D}$ saturates (i.e., stays constant as $v_{D S}$ is increased further). We find this value of $v_{D S}$ by determining when $\partial i_{D} / \partial v_{D S}$ is zero. Doing this yields

$$
\begin{equation*}
v_{D S, \text { sat }}=L \mathscr{E}_{\text {crit }}\left[\sqrt{1+\frac{2\left(v_{G S}-V_{T}\right)}{L_{\mathscr{G}}^{\mathscr{C r i t}}}}-1\right] \tag{10.32}
\end{equation*}
$$

The behavior predicted by this model is illustrated in Fig. 10.10, where we plot Eq. (10.31b) for a device for which $K$ is $0.1 \mathrm{~mA} / \mathrm{V}^{2}, L_{\mathscr{C}_{\text {crit }}}$ is 2 V , and $V_{T}$ is 0.5 V . A family of curves is plotted for $v_{G S}$ equal to $1,2,3,4$, and 5 V .

At first glance the characteristics in Fig. 10.10 look very similar to other MOSFET characteristics we have seen, but closer examination shows that there are important differences. First, the saturation voltage is less than ( $v_{G S}-V_{T}$ ), especially when $\left(v_{G S}-V_{T}\right)$ is large, as in the curves for $v_{G S}=3,4$, and 5 V . For example, when $\left(v_{G S}-V_{T}\right)$ is $0.5 \mathrm{~V}, v_{D S, \text { sat }}$ is 0.45 V (i.e., they are similar). However when $\left(v_{G S}-V_{T}\right)$ is $1.5 \mathrm{~V}, v_{D S, \text { sat }}$ is only 1.16 V , and the difference increases as ( $v_{G S}-V_{T}$ ) increases. We find that $v_{D S, \text { sat }}$ is approximately $1.75,2.25$, and 2.7 V when $\left(v_{G S}-V_{T}\right)$ is $2.5,3.5$, and 4.5 V , respectively.

Second, the saturation current is lower. In our model without velocity saturation, $i_{D, \text { sat }}$ is $K\left(v_{G S}-V_{T}\right)^{2} / 2$. Thus when $\left(v_{G S}-V_{T}\right)$ is 4.5 V we would expect the saturation current to be 2 mA . In Fig. 10.10 it is less than 0.4 mA !

To explore these characteristics more, it is most instructive to consider two situations. The first is when $L$ and/or $\mathscr{E}_{\text {crit }}$ is relatively large and the product $L_{\mathscr{E}_{\text {crit }}}$ is appreciably larger (by a factor of 2 or more) than $\left(v_{G S}-V_{T}\right)$. In this case we have our earlier result; that is,

$$
\begin{equation*}
v_{D S, \text { sat }} \approx\left(v_{G S}-v_{T}\right) \tag{10.33}
\end{equation*}
$$



FIGURE 10.10
Output characteristic family for a MOSFET in which velocity saturation is a factor. Velocity saturation is not important for the $v_{G S}=1 \mathrm{~V}$ curve, it plays a modest role in the $v_{G S}=2 \mathrm{~V}$ curve, and it is a major factor in the $v_{G S}=3,4$, and 5 V curves.
and $i_{D}$ saturates at

$$
\begin{equation*}
i_{D, \text { sat }}=\frac{1}{1+\left(v_{G S}-V_{T}\right) / L^{\mathscr{G}} \text { crit }} \frac{K}{2}\left(v_{G S}-V_{T}\right)^{2} \tag{10.34a}
\end{equation*}
$$

From Eq. (10.34a), we see that the first impact of velocity saturation is to lower the current of a MOSFET in saturation. How much it is lowered depends on how large the factor $\left(v_{G S}-V_{T}\right) / L_{\mathscr{E}_{\text {crit }}}$ is.

Another way of looking at this $i_{D, \text { sat }}$ result is obtained by substituting our expression for $K$ into Eq. (10.34a). Doing this and writing $\mu_{e} \mathscr{E}_{\text {crit }}$ as $s_{\text {sat }}$, the velocity at which the electrons in the channel saturate when $\mathscr{E}_{y}$ is much greater than $\mathscr{E}_{\text {crit }}$, we obtain

$$
\begin{equation*}
i_{D, \text { sat }}=\frac{W s_{\mathrm{sat}} C_{\mathrm{oX}}^{*}}{2\left[\left(v_{G S}-V_{T}\right)+L \mathscr{E}_{\mathrm{crit}}\right]}\left(v_{G S}-V_{T}\right)^{2} \tag{10.34b}
\end{equation*}
$$

Written this way, the reduced sensitivity of $i_{D, \text { sat }}$ to $\left(v_{G S}-V_{T}\right)$ is a bit clearer and the virtue of a large $s_{\text {sat }}$ is certainly apparent.

When the channel length $L$ is very short, and/or $\mathscr{E}_{\text {crit }}$ is small so that the product $L \mathscr{E}_{\text {crit }}$ is smaller than $\left(v_{G S}-V_{T}\right)$, then $V_{D S, \text { sat }}$ takes a much different value. Returning to Eq. (10.32), we find now that

$$
\begin{equation*}
v_{\mathrm{DS}, \mathrm{sat}} \approx \sqrt{2\left(v_{G S}-V_{T}\right) L^{\mathscr{C}} \mathrm{Crit}}{ }^{-L_{\mathrm{crit}}} \tag{10.35}
\end{equation*}
$$

and $i_{D}$ saturates at

$$
\begin{equation*}
i_{D, \text { sat }} \approx K L \mathscr{E}_{\mathrm{crit}}\left[v_{G S}-V_{T}-\sqrt{\frac{\left(v_{G S}-V_{T}\right) L \mathscr{G}_{\mathrm{crit}}}{2}}\right] \tag{10.36}
\end{equation*}
$$

This characteristic is much different than one that we find in a device in which velocity saturation is not significant. The family of curves of $i_{D}$ versus $v_{D S}$ for different values of $v_{G S}$ saturate at a voltage that increases more nearly as $\sqrt{\left(v_{G S}-V_{T}\right)}$, rather than linearly with $\left(v_{G S}-V_{T}\right)$. The saturation current $i_{D, \text { sat }}$ increases at best linearly with $\left(v_{G S}-V_{T}\right)$, rather than as $\left(v_{G S}-V_{T}\right)^{2}$. These features are evident in Fig. 10.10, which corresponds to the present limit when $v_{G S}$ is 4 and 5 V .

In summary, we have shown that both the saturation voltage and saturation current are lower than when velocity saturation is not considered. This is actually a good result as far as the saturation voltage is concerned; a low saturation voltage is desirable. The fact that the saturation current is lower is not so good, however, because we like to get as much current as we can from a device at a given voltage. Another important factor to note in Fig. 10.10 is that the weaker dependence of $i_{D, \text { sat }}$ on $\left(v_{G S}-V_{T}\right)$ means that the family of $\left(i_{D, \text { sat }}-v_{D S}\right)$ curves for equal ( $v_{G S}-V_{T}$ ) increments are more closely and evenly spaced. This is equivalent to saying that the small-signal transconductance $g_{m}$ is reduced and is less sensitive to bias points in the extreme of severe velocity saturation (i.e., when Eq. (10.36) holds).

Finally, before leaving this issue it makes sense to look at a few more numbers. For example, we said above that $\mathscr{E}_{\text {crit }}$ in the channel of a silicon MOSFET is on the order of $5 \times 10^{4} \mathrm{~V} / \mathrm{cm}$. If the channel length $L$ is $2 \mu \mathrm{~m}$, then the product $L \mathscr{E}_{\text {crit }}$ is 10 V and velocity saturation is not an issue, certainly not in most digital circuits where supply voltages are between 3 and $5 \mathrm{~V}(5 \mathrm{~V}$ in older circuits with longer gate lengths; down to 3 V or even 2 V in newer circuits with submicron gate lengths). If, however, $L$ is reduced to $0.5 \mu \mathrm{~m}$, the $L_{\mathscr{E}_{\text {crit }}}$ product is 2.5 V and velocity saturation begins to be a factor. As $L$ gets even smaller, velocity saturation can be a dominant factor.
d) Dynamic models with charge stores. To make our MOSFET model suitable for dynamic analyses we must examine the device structure and identify the energy storage elements (primarily capacitances) that we must add to our model. Two representative MOSFET device structures are shown in cross section in Fig. 10.11. The first structure, Fig. 10.11a, is a device built using what is called a metal-gate technology. This technology necessitates a considerable overlap of the gate metal and the diffused source and drain $n^{+}$-regions. The second structure, shown in Fig. $10.11 b$, is a self-aligned, silicon-gate structure, which uses heavily doped, polycrystalline silicon as the gate "metal" to eliminate this overlap. The use of silicon for the gate permits the source and drain region edges to be aligned with the edges of the gate during fabrication of the device.

Looking at the device structures of Fig. 10.11 to identify capacitances, we see that there are several. Clearly the gate electrode is a large capacitor plate, so there should be a capacitance between the gate and the channel and there should be additional capacitance because of the overlap of the gate metal and the $n^{+}$ source and drain diffusions. Finally, there must be capacitance associated with the source and drain $n^{+}$-regions.


FIGURE 10.11
Cross-sectional drawings of two MOSFET structures: (a) metal-gate; and (b) self-aligned silicon-gate.

The gate-to-channel capacitance actually deserves very careful attention. Although it is clear that the charge on the gate enters through the gate electrode, it is less clear whether the charge in the inversion layer enters through the source or the drain electrode. In saturation the drain electrode is decoupled from the source and gate as far as the intrinsic device operation is concerned, so any change in the inversion layer charge can be supplied only by the source. Any gate-to-drain capacitance in saturation must therefore be only that due to any physical overlap of the gate metal and the drain $n^{+}$-region. In the linear, or triode, region, however, a significant fraction of the channel charge can come through the drain and a correspondingly larger fraction of the gate capacitance must appear between the gate and drain.

These arguments can be quantified by writing an expression for the total gate charge and examining its dependence on the gate-to-source and gate-todrain voltages. Rather than take the time to do this now, however, we will defer the calculation of $q_{G}\left(v_{G S}, v_{G D}\right)$ to Sec. 14.3.2* and simply note here that these

[^7]intrinsic contributions to the gate charge are, in general, nonlinear functions of the voltages involved; in addition, they are, in general, proportional to the gate area $W L$ and the oxide capacitance per unit area, $C_{o x}^{*},\left(=\varepsilon_{o} / t_{o}\right)$.

Returning now to our dynamic large-signal model, we can add nonlinear capacitors representing the four charge stores we have identified-one each between the gate and source and between the gate and drain, and one each associated with the source-to-substrate and the drain-to-substrate $n^{+}-p$ junctions. With these additions our model becomes as illustrated in Fig. 10.12. For completeness, we used our most complex MOSFET model for this figure; you should be able to add these nonlinear capacitors to the simpler model of Fig. 10.7 yourself.

### 10.1.2 Static Small-Signal Linear Model

The development of a small-signal linear model for MOSFETs follows the same reasoning that we used for diodes and bipolar junction transistors. The only change is that now we have four terminals, so we must model three independent terminal currents in terms of three independent terminal voltages. We will look at two connections, common-source and common-gate.
a) Common-source. In the common-source connection, we want to find linear relationships for the small-signal gate, back gate, and drain currents ( $i_{g}, i_{b}$, and $i_{d}$, respectively) in terms of the small-signal gate-to-source, back-to-source, and drain-to-source voltages ( $\nu_{g s}, v_{b s}$, and $v_{d s}$, respectively). Since the gate and back currents are zero in our large-signal model, they remain zero for small-signal voltages:

$$
\begin{align*}
& i_{g}=0  \tag{10.37a}\\
& i_{b}=0 \tag{10.37b}
\end{align*}
$$

assuming a bias point such that $V_{D S} \geq 0$ and $V_{B S} \leq 0$. The drain current, on the other hand, is in general not zero and may depend on all three terminal voltages. We can write

$$
\begin{equation*}
i_{d}=g_{m} v_{g s}+g_{m b} v_{b s}+g_{o} v_{d s} \tag{10.37c}
\end{equation*}
$$

where we define the various conductances as follows:

$$
\begin{array}{r}
\text { Forward transconductance, }\left.g_{m} \equiv \frac{\partial i_{D}}{\partial v_{G S}}\right|_{Q} \\
\text { Substrate transconductance, }\left.g_{m b} \equiv \frac{\partial i_{D}}{\partial v_{B S}}\right|_{Q} \\
\text { Output conductance, }\left.g_{o} \equiv \frac{\partial i_{D}}{\partial v_{D S}}\right|_{Q} \tag{10.40}
\end{array}
$$



FIGURE 10.12
MOFSET circuit model from Fig. 10.9 with the addition of nonlinear charge stores to account for the gate charge and for the junctions between the source and drain $n^{+}$-regions and the substrate.

The corresponding small-signal model is illustrated in Fig. 10.13. This model is the same for both $n$ - and $p$-channel MOSFETs.

We next use our large-signal model to evaluate the three parameters in the small-signal model. We will assume an $n$-channel device for purposes of discussion, but the results can be used for either type of device. The parameter values will depend on the bias point, and the expressions for them will depend upon the region in which the device is biased. In cutoff, $V_{G S}<V_{T}$, we find that all currents are zero, so $g_{m}=g_{m b}=g_{0}=0$. In saturation, $0 \leq\left(V_{G S}-V_{T}\right) \leq V_{D S}$, we see from Eq . ( 10.15 b ) that

$$
\begin{align*}
g_{0} & =0  \tag{10.41}\\
g_{m} & =K\left(\left|V_{G S}-V_{T}\right|\right) \tag{10.42a}
\end{align*}
$$

or, equivalently,

$y_{b s}$


FIGURE 10.13
Small-signal equivalent circuit for the MOSFET. This model is restricted to operation about a bias point for which $V_{B S} \leq 0$ and $V_{D S} \geq 0$.

$$
\begin{equation*}
g_{m}=\left(2 K\left|I_{D}\right|\right)^{1 / 2} \tag{10.42b}
\end{equation*}
$$

and

$$
\begin{equation*}
g_{m b}=\eta g_{m} \tag{10.43}
\end{equation*}
$$

where we have defined $\eta$ as

$$
\begin{equation*}
\eta \equiv-\left.\frac{\partial V_{T}}{\partial v_{B S}}\right|_{\varrho} \tag{10.44}
\end{equation*}
$$

In practice we find that $\eta$ is a positive number whose magnitude is typically on the order of 0.03 to 0.1 .

The conclusion that the output conductance $g_{o}$ is zero in saturation is a consequence of our assumption that the current truly saturates above a drain-tosource voltage of ( $v_{G S}-V_{T}$ ). Often, however, the width of the region near the drain over which the channel has disappeared increases slightly as $v_{D S}$ is increased above $\left(v_{G S}-V_{T}\right)$. This reduces the effective length of the channel slightly, leading to a small increase of drain current in saturation and thus to a very small, but finite, output conductance for bias points in the saturation region. This is illustrated in Fig. 10.14. The analogous effect with bipolar transistors was the Early effect, or base width modulation. For MOSFETs, too, we define an Early voltage and use it to calculate the output conductance at any bias point, as is also illustrated in Fig. 10.14. We have, assuming that $\left|V_{A}\right| \gg V_{D S}$,

$$
\begin{equation*}
g_{o} \approx\left|\frac{I_{D}}{V_{A}}\right| \tag{10.45}
\end{equation*}
$$

An important observation is that in MOSFETs, as a general rule, the Early voltage scales with the gate length $L$. That is, the Early voltages $V_{A 1}$ and $V_{A 2}$ of two otherwise identical devices with different gate lengths $L_{1}$ and $L_{2}$ will be related approximately as

$$
\begin{equation*}
\frac{V_{A 1}}{V_{A 2}} \approx \frac{L_{1}}{L_{2}} \tag{10.46}
\end{equation*}
$$



FIGURE 10.14
Output characteristics of a MOSFET in the forward active region extrapolated back to intersect the horizontal axis at the Early voltage $V_{A}$.

The Early voltage of a device does not scale with the device width; that is, two otherwise identical devices with different gate widths will have the same Early voltage.

Finally, in the linear region, $0 \leq V_{D S} \leq\left(V_{G S}-V_{T}\right)$, we find

$$
\begin{align*}
g_{o} & =K\left(\left|V_{G S}-V_{T}-V_{D S}\right|\right)  \tag{10.47}\\
g_{m} & =\left|K V_{D S}\right|  \tag{10.48}\\
g_{m b} & =\eta g_{m} \tag{10.49}
\end{align*}
$$

We can notice immediately that in the linear region the output conductance $g_{o}$ is nonzero, even in the ideal device. Notice also that the transconductance $g_{m}$ is lower than it was in the saturation region.

## Example

Question. Find the small-signal equivalent circuit for the MOSFET in the preceding example for operation about the gate-to-source bias voltage specified there (i.e., $V_{G S}=2 \mathrm{~V}$ ) and assuming (a) $V_{D S}$ is 0.5 V , and (b) $V_{D S}$ is 4 V .

Discussion. We first note that since $\left(V_{G S}-V_{T}\right)$ is 1.35 V , the transistor is biased in the linear, or triode, region in (a) and is saturated in (b).

With the MOSFET biased in the linear region with $V_{D S}=0.5 \mathrm{~V}$, we find by using Eqs. (10.48) and (10.47) that $g_{n}$ is 0.60 mS and that $g_{0}$ is 0.55 mS . This latter value corresponds to an output resistance $r_{0}\left(=1 / g_{0}\right)$ of $1.8 \mathrm{k} \Omega$.

With the MOSFET biased in saturation, $g_{o}$ is identically zero according to our model and we find from either Eqs. (10.42a) or (10.42b) that 8 m is 1.35 mS .

The transconductance $g_{m}$ of the MOSFET is considerably smaller than that of a bipolar junction transistor (BJT) biased at the same output current level; that is, $g_{m}$ (BJT), which equals $q I_{C} / k T$, is 36 mS if $I_{C}$ is 0.9 mA . This is again a fairly typical result, and a large transconductance is not the reason circuit designers are attracted to MOSFETs. Often a far more significant feature is MOSFETs' extremely high input resistance.

Thus far we have ignored $g_{m b}$, which is related to $g_{m}$ through the factor $\eta$. To calculate $\eta$ we return to Eq. (10.12c) for $V_{T}\left(v_{B S}\right)$ and calculate $-\partial V_{T} /\left.\partial v_{B S}\right|_{Q}$.

Doing this we find

$$
\begin{equation*}
\eta=\frac{t_{0}}{\varepsilon_{o}} \sqrt{\frac{\varepsilon_{S i} q N_{A}}{2\left(\left|2 \phi_{p}\right|-v_{B S}\right)}} \tag{10.50}
\end{equation*}
$$

which, for the particular MOSFET we are considering, turns out to be a relatively large 0.34 . Notice that $\eta$ is related to the body effect coefficient $\gamma$ as

$$
\begin{equation*}
\eta=\frac{\gamma}{2 \sqrt{\left|2 \phi_{p}\right|-v_{B S}}} \tag{10.51}
\end{equation*}
$$

Notice also that $\eta$ is equivalent to the parameter $\alpha$ we introduced in Eq. (10.23).
Before leaving the quasistatic common-source small signal model, it is appropriate to make a few comments about the impact on circuit analysis problems of having to deal with the back-gate, or substrate, transconductance current source, $g_{m b} v_{b s}$. Having this additional dependent source at first appears to complicate our model and analysis enormously compared to what we had with a bipolar junction transistor. In practice, however, the situation is usually quite different. In many circuits the substrate is either connected directly to the source or is at a fixed bias relative to the source, so that $v_{b s}$ is zero and the $g_{m b} v_{b s}$ generator does not enter the picture. The small-signal equivalent circuit is then as shown in Fig. 10.15a.

In many other circuits, the substrate is incrementally connected to the drain, so $v_{b s}$ is equal to $v_{d s}$. In this case the $g_{m b} v_{b s}$ generator is equivalent to a transconductance in parallel with $g_{o}$ and the equivalent circuit becomes that illustrated in Fig. 10.15b. Again the resulting circuit is no more complicated than that of a BJT.
b) Common-gate. Sometimes it is desirable to have a linear incremental circuit model for the MOSFET that has a common-gate topology, rather than a common-


FIGURE 10.15
Small-signal linear equivalent circuit models for MOSFETs in two special common-source situations: (a) when $v_{b s}=0$;
(b) when $v_{b s}=v_{d s}$.
source topology like the model we just discussed (see Fig. 10.15). In this case we want a model in which $i_{s}$ and $i_{d}$ are viewed as the input and output currents, respectively, and are written as functions of $v_{s g}, v_{d g}$, and $v_{b g}$. One way to get this model is to begin with our low-frequency common-source model, Fig. 10.13, and write the current expressions

$$
\begin{align*}
& i_{g}=0  \tag{10.52}\\
& i_{b}=0  \tag{10.53}\\
& i_{d}=g_{m} v_{g s}+g_{m b} v_{b s} \tag{10.54}
\end{align*}
$$

Note that we have assumed a bias point in saturation and that $g_{o} \approx 0$ (we will consider later what happens when $g_{0}$ cannot be neglected). We then solve for $i_{s}$, using the fact that $i_{g}, i_{d}, i_{b}$, and $i_{s}$ must sum to zero. Since $i_{g}$ and $i_{b}$ are themselves zero, the result is very simple and powerful. We have simply

$$
\begin{equation*}
i_{s}=-i_{d} \tag{10.55a}
\end{equation*}
$$

That is, what goes in the input comes out the output (while at the same time, as we shall see, what happens at the output does not affect the input). In terms of terminal voltages this is

$$
\begin{equation*}
i_{s}=-g_{m} v_{g s}-g_{m b} v_{b s} \tag{10.55b}
\end{equation*}
$$

Our next step is to write this equation in terms of the terminal voltages referenced to the gate (i.e., $v_{s g}, v_{b g}$, and $v_{d g}$ ). Recognizing that $v_{g s}$ is $-v_{s g}, v_{b s}$ is ( $v_{b g}-v_{s g}$ ), and $v_{d s}$ is $\left(v_{d g}-v_{s g}\right)$, and substituting these in Eq. (10.55b) we find

$$
\begin{align*}
& i_{s}=\left(g_{m}+g_{m b}\right) v_{s g}-g_{m b} v_{b s}  \tag{10.55c}\\
& i_{d}=-i_{s}=-\left(g_{m}+g_{m b}\right) v_{s g}+g_{m b} v_{b g} \tag{10.56}
\end{align*}
$$

A circuit model representing these expressions is illustrated in Fig. 10.16. Note that we have made use of the fact that $\left(g_{m}+g_{m b}\right)$ can be written more conveniently as $g_{m}(1+\eta)$.

You will notice that in Fig. 10.16a we have chosen to write $i_{d}$ in terms of its dependence on the terminal voltages rather than simply saying that it is $-i_{s}$. This deserves a bit of discussion. First, it is very powerful to observe that $i_{d}$ is $-i_{s}$ and thus that the common-gate topology operates with a unity current gain and as what could be termed a current-follower (analogous to the voltage-follower operation of the source-follower circuit discussed in Sec. 11.4.4). This is how you should view the common-gate circuit when you consider applications of this topology.

On the other hand, when we start adding parasitics to our model to extend the model to high frequencies, or $g_{0}$ to account for a finite output conductance, the identity of $i_{s}$ tends to get lost, just as the identity of $i_{b}$ got lost in the high frequency hybrid- $\pi$ model (see Sec. 8.2.3). In this case it becomes desirable to have a model dependent on quantities - the terminal voltages, in this case-whose identities remain unambiguous.


FIGURE 10.16
Linear incremental equivalent circuit models for the MOSFET in a common-gate configuration: (a) the full model with an arbitrary voltage signal on the substrate lead b ; (b) the model relevant when, as is often the case, $v_{b g}$ is zero. The latter model is much simpler than the first and is the one most commonly used in initial designs with the common-gate stage.

Having said all this, let us now return to the model of Fig. 10.16a and discuss it a bit more. First we note that in many common-gate applications both the gate and substrate are incrementally grounded so that $v_{b g}$ is zero. In such cases the model of Fig. $10.16 b$ results. For many applications, and certainly for a "first cut," this model is ideal for visualizing what the common-gate topology will do, which may be described as follows: First, as we said earlier, it has unity current gain. Second, it has very low input impedance. Conceptually, then, it can be used to sense a current in a lead without disturbing the circuit (i.e., it adds very little resistance), and it can transmit an identical current to an "arbitrary" load.* We will discuss the common-gate amplifier circuit at some length in Sec. 11.4.3.

Looking next at the issue of output conductance, we find that $g_{o}$ appears between the drain and source, as shown in Fig. 10.17a. In this position, if we

[^8]look into the input terminals (the source and gate), the output conductance looks like an effective conductance of value $g_{o}\left[1-g_{m}(1+\eta) / G_{L}\right]$, where $G_{L}$ is the conductance of the load, in parallel with the physical conductance $g_{m}(1+\eta)$. The effective conductance depends on the load on the transistors; thus, unlike the other equivalent circuits we have developed so far, this model depends very much on the circuit in which it is being used. You can see this by calculating the input resistance at the input terminals. At the output it looks like a conductance of value $g_{o}$ in parallel with the load.* These equivalences are illustrated in Fig. 10.17b. An important feature of this model, and the main reason for deriving it, is that there are now no elements coupling the output back to the input. This makes our analysis easier and lets us see what the effective coupling really is.

The factor $g_{o}\left[1-g_{m}(1+\eta) / G_{L}\right]$ in the input conductance term is worth a few words. We shall see in Chap. 11 that $g_{m}(1+\eta) / G_{L}$ is the mid-band voltage gain of this common-gate stage and that this factor is thus undoubtedly much greater than 1 . If this is the case, the entire term, $g_{0}\left[1-g_{m}(1+\eta) / G_{L}\right]$, will be negative. This means that the total input conductance is now smaller, and the input resistance larger, than if $g o$ were zero. Usually, making the input resistance


FIGURE 10.17
Effects of accounting for a nonzero output conductance on the common-gate linear incremental equivalent circuit: (a) a model for which the output conductance $g_{0}$ is simply added between the drain and source, which is where it appears physically; $(b)$ the equivalent conductances that bridge the input and output terminals incorporated in a model in which there is no longer an element that couples the output back to the input.
*The exact value is $g_{0}\left(g_{m}-G_{L}\right) /\left(g_{m}+g_{o}\right)$, which is essentially $g_{0}$.
larger is a very desirable result, but in this case it is not because a major reason for using the common-gate topology is to get a low input resistance. It is somehow reassuring to find that a parasitic element (i.e., $g_{o}$ ) can do no good; if it had turned out differently we would have had to be very suspicious that we had made a mistake.

The observation that the effective input conductance is related to the voltage gain of the stage is a general consequence of the fact that the element $g_{o}$ is coupling, or feeding back, output signal to the input. This is termed the Miller effect. We will study this effect at length in Chap. 14 when we discuss the highfrequency performance of our circuits.
c) High-Frequency Small-Signal Model. To extend our small-signal MOSFET model to high frequencies we must examine the device structure shown in Fig. 10.11 and identify the energy storage elements (primarily capacitances) that we must add to our model, just as we did in Sec. 10.1.1d when we developed our dynamic large-signal model. Equivalently, we can look directly at the dynamic model in Fig. 10.12 and replace the nonlinear charge stores with their linear equivalent capacitors valid for the particular bias point in question. For either approach, we see immediately that there is significant capacitance between the gate and the source due primarily to the MOS gate electrode structure; we call this capacitor $C_{g s}$. There is also capacitance between the gate and the drain; that is, the gate charge depends on $v_{G D}$ as well as on $v_{G S}$, at least when the device is not saturated. In saturation the channel is ideally decoupled from the drain, and the gate-to-drain capacitance, which we call $C_{g d}$, is ideally zero. In a real transistor, however, $C_{g d}$ is not zero (although it can be very small) because of the inevitable physical coupling between the gate electrode and the drain $n^{+}$-region and contact.

This discussion can be quantified and $C_{g s}$ and $C_{g d}$ can be modeled by writing an expression for the gate charge $q_{G}$ as a function of the terminal voltages and taking the appropriate derivatives. That is,

$$
\begin{equation*}
\left.C_{g s} \equiv \frac{\partial q_{G}}{\partial v_{G S}}\right|_{Q} \tag{10.57a}
\end{equation*}
$$

and

$$
\begin{equation*}
\left.C_{g d} \equiv \frac{\partial q_{G}}{\partial v_{G D}}\right|_{Q} \tag{10.57b}
\end{equation*}
$$

We will not do this here; rather, we defer the calculation of $C_{g s}$ and $C_{g d}$ until we need expressions for them in Chap. 14.*

There must also be capacitances between the source and substrate, between the gate and substrate, and between the drain and substrate, due in part to the
*See footnote in Sec. 10.1.1d.


FIGURE 10.18
(a) Small-signal common-source equivalent circuit MOSFET model of Fig. 10.8 modified for high-frequency applications by the addition of small-signal parasitic capacitances; (b) the common-gate incremental circuit ( $v_{b g}=0$ ) with the parasitic gate-to-drain, gate-to-source, substrate-to-drain, and substrate-to-source capacitances added.
respective $n^{+}-p$ junctions and in part to the depletion region charge under the channel. We denote these capacitors as $C_{s b}, C_{g b}$, and $C_{d b}$, respectively. All of these capacitances are shown added to our small-signal common-source model in Fig. 10.18a. Similarly, the common-gate incremental circuit model with the parasitic capacitances added is shown in Fig. $10.18 b$ (in drawing this circuit we have taken $v_{b g}$ to be zero). Notice that in the common-gate circuit there are no capacitors connecting the input and output as there are in the common-source circuit; this is an important feature of this circuit, as we shall see in Chap. 14.

### 10.2 JUNCTION FIELD EFFECT <br> TRANSISTORS

Another important field effect transistor is the junction field effect transistor, or JFET. A typical JFET device structure is illustrated in Fig. 10.19. This device uses the fact that by changing the bias voltage on the gate junction diode, one can change its depletion region width and thereby change the width of the conducting channel between the source and the drain. This in turn controls the amount of current flowing through the device. This is a very simple concept but an extremely powerful one.


FIGURE 10.19
Cross-sectional drawing of a typical $n$-channel junction field effect transistor. This structure is used in the derivation of the large-signal JFET model in the text.

When the voltage difference between the drain and source is small and the drain-to-source current is small, the widths of the depletion region and of the conducting channel are essentially uniform, as illustrated in Fig. 10.20a, and the drain current $i_{D}$ increases approximately linearly with $v_{D S}$. This is illustrated in Fig. $10.20 e$. As the drain-to-source voltage and current increase further, however, the reverse bias on the gate junction and the depletion region width increase appreciably moving from the source to drain, as illustrated in Fig. 10.20b, and the increase of $i_{D}$ is sublinear with $v_{D S}$, as shown in Fig. 10.20e. Eventually the depletion region at the drain end of the channel will completely pinch off the conducting channel, as illustrated in Fig. $10.20 c$, and the current will saturate just as it does in a MOSFET, as shown in Fig. 10.20e. If the gate-to-source bias is too negative, the depletion region, even with no drain-to-source voltage, will extend throughout the channel and completely block conduction between the drain and source, as shown in Fig. 10.20d. In this condition, no current will flow for any drain bias, as illustrated in Fig. $10.20 e$. The terminal behavior and modes of operation are very much similar to those of a MOSFET.

We will begin our analysis of JFETs by developing a large-signal description for the terminal behavior of these devices. Then we will develop small-signal models based on this large-signal model.

### 10.2.1 Large-Signal Model

We now turn to the problem of modeling the drain, gate, and substrate (or back) currents ( $i_{D}, i_{G}$, and $i_{B}$, respectively) for the JFET illustrated in Fig. 10.19 as functions of the drain-to-source, gate-to-source, and back-to-source voltages ( $v_{D S}, v_{G S}$, and $v_{B S}$, respectively). As we did with the MOSFET, we will limit the terminal voltages to certain useful bias ranges rather than attempting to model


FIGURE 10.20
Illustrations of the depletion region shape in the channel region of a JFET under different bias conditions: (a) near the origin: $v_{p}<v_{G S}<0, v_{D S}$ very small, $v_{B S}=0$; (b) in the linear region: $V_{p}<v_{G S}<0, v_{D S}$ appreciable; (c) saturation: $V_{p}<v_{G S}<0$, $v_{D S}>\left(v_{G S}-V_{p}\right) ;(d)$ cutoff: $v_{G S}<V_{p} ;(e)$ current-voltage characteristics corresponding to the bias and depletion region conditions illusrated in (a) through (d),
the terminal currents for arbitrary terminal voltages. This makes our modeling task much easier, to be sure, but it is also all we really care about since the device is only useful when biased properly.

We first restrict ourselves to biases such that the lower $p$ - $n$ junction, the substrate-to-channel junction, is never forward-biased. Just as we did when modeling the $n$-channel MOSFET, we restrict our model to $v_{B S} \leq 0$ and $v_{D S} \geq 0$. With this restriction the substrate current is negligible (i.e., $i_{B} \approx 0$ ).

Next we restrict ourselves to operation where the gate current is negligible (i.e., $i_{G} \approx 0$ ) by requiring that $v_{G S} \leq V_{O N}$, where $V_{O N}$ is the forward-bias voltage -above which this junction conducts appreciably. We use the bound $V_{O N}$ rather than zero in anticipation of the fact that it will in some instances be useful to slightly forward-bias the upper $p-n$ junction, the gate-to-channel junction. As long as the forward bias is small, the junction current will still be negligible.

When $i_{B}$ and $i_{G}$ are negligible, we have only one current, the drain current $i_{D}$, to deal with. Our approach to relating $i_{D}$ to $v_{D S}, v_{G S}$, and $v_{B S}$ will be similar to the one we used with the MOSFET. We relate the current density at any point in the channel to the electric field at that point, $\mathscr{E}_{y}$; and to the number of charge carriers in the channel, their charge, and their mobility. Doing this we will obtain an expression that can be integrated from one end of the channel to the other to yield $i_{D}\left(v_{D S}, v_{G S}, v_{B S}\right)$.

To proceed we first assume that the electric field and current flow in the channel are entirely horizontal (i.e., in the $y$-direction only). Clearly this is an approximation because if the channel becomes wider moving from the drain to the source (see Figs. $10.20 b$ and $c$ ) there must be some component of the current (and field) in the $x$-direction. But if the rate at which the width of the channel increases is sufficiently small (i.e., if the channel is sufficiently gradual), the $x$-component will be negligible. This is the gradual channel approximation in the context of the JFET.

Using the gradual channel approximation, the voltage in the channel, $v_{C S}$, is a function only of $y$. At any position $y$ along the channel, the voltage relative to the source is $v_{C S}(y)$ and the electric field $\varepsilon_{y}(y)$ is $-\partial v_{C S} /\left.\partial y\right|_{y}$. We will further assume that there are negligible voltage drops between the source and the drain contacts and the ends of the channel at $y=0$ and $y=L$. We thus have

$$
\begin{align*}
& v_{C S}(L)=v_{D S}  \tag{10.58a}\\
& v_{C S}(0)=0 \tag{10.58b}
\end{align*}
$$

The current in the channel, $i_{D}$, is the drift current density in the channel, $-q \mu_{e} N_{D} \mathscr{E}_{y}$, multiplied by the cross-sectional area of the channel, $\left[a-x_{D}(y)\right] Z$, where $a$ is the distance between the upper and lower $p-n$ junctions and $x_{D}(y)$ is the sum at $y$ of the depletion region widths on the $n$-sides (i.e., channel sides) of the upper and lower $p-n$ junctions. $Z$ is the extent of the device in the $z$-direction (i.e., normal to the cross section in Fig. 10.19). Thus

$$
\begin{equation*}
i_{D}=Z \mu_{e} q N_{D}\left[a-x_{D}(y)\right] \frac{d v_{C S}(y)}{d y} \tag{10.59}
\end{equation*}
$$

You may want to compare this equation to Eq. (10.4) for the MOSFET; these results are analogous.

The next step is to relate the total depletion region width $x_{D}(y)$ to the voltage in the channel, $v_{C S}(y)$. Again we make use of the gradual channel approximation and say that at any point $y$ we can assume that the electric field in the depletion region is entirely vertical (i.e., solely in the $x$-direction). We then use the depletion approximation to solve for the depletion region widths at each junction.

We will assume that the device we are modeling is built with the $n$-type channel region much more heavily doped than the substrate. Thus the width of the depletion region on the channel side (i.e., the $n$-side) of this junction is negligible. As a result, $x_{D}(y)$ is essentially just the $n$-side depletion region width of the upper $p-n$ junction. At any point $y$, the bias applied to the junction, $v_{G C}(y)$, is $v_{G S}-v_{C S}(y)$. Using this we have

$$
\begin{equation*}
x_{D}(y) \approx \sqrt{\frac{2 \varepsilon_{S i} N_{A p}\left[\phi_{b}-v_{G S}+v_{C S}(y)\right]}{q N_{D n}\left(N_{D n}+N_{A p}\right)}} \tag{10.60a}
\end{equation*}
$$

In a well-designed JFET, the $p^{+}$gate region is more heavily doped than the channel region (i.e., $N_{A p} \gg N_{D_{n}}$ ), so that the depletion region at the upper junction extends primarily into the channel. In this case we can use the approximation

$$
\begin{equation*}
x_{D}(y) \approx \sqrt{\frac{2 \varepsilon_{\mathrm{Si}}\left[\phi_{b}-v_{G S}+v_{C S}(y)\right]}{q N_{D n}}} \tag{10.60b}
\end{equation*}
$$

We are now ready to complete our derivation. We insert Eq. (10.60b) into Eq. (10.59) and integrate from $y=0$ to $y=L$, or equivalently from $v_{C S}=0$ to $v_{C S}=v_{D S}$, just as we did for the MOSFET. The result is
$i_{D}=a \frac{Z}{L} q \mu_{e} N_{D n}\left\{v_{D S}-\frac{2}{3} \sqrt{\frac{2 \varepsilon_{S i}}{q N_{D n} a^{2}}}\left[\left(\phi_{b}-v_{G S}+v_{D S}\right)^{3 / 2}-\left(\phi_{b}-v_{G S}\right)^{3 / 2}\right]\right\}$

This expression is plotted in Fig. 10.21 for a representative JFET.
Equation (10.61) is valid as long as the depletion region width $x_{D}(y)$ is less than $a$. If $x_{D}(y)$ is equal to or greater than $a$ at some position between 0 and $L$, we must modify our expression. There are two circumstances where this occurs. The first is when the gate junction is sufficiently reverse-biased that the channel is fully depleted over all its length, as was illustrated in Fig. 10.20d. The gate voltage at which $x_{D}=a$ is called the pinchoff voltage $V_{P}$. Thus

$$
\begin{equation*}
V_{P} \equiv-\frac{q N_{D n} a^{2}}{2 \varepsilon_{\mathrm{Si}}}+\phi_{b} \tag{10.62}
\end{equation*}
$$

If $v_{G S} \leq V_{P}$, then the JFET channel is fully pinched off and the drain current is zero:

$$
\begin{equation*}
i_{D}=0 \quad \text { for } v_{G S} \leq V_{P} \tag{10.63}
\end{equation*}
$$

The second circumstance in which the channel disappears occurs when the drain-to-source voltage is sufficiently large that the depletion region at the drain end of the channel is $a$ or larger, as was illustrated in Fig. 10.20c. This occurs whenever $v_{G D}$ is less than $V_{P}$, which in terms of $v_{D S}$ is

$$
\begin{equation*}
v_{D S} \geq v_{G S}-V_{P} \tag{10.64}
\end{equation*}
$$



FIGURE 10.21
Drain current expression, Eq. (10.61), plotted for a Si device in which $\phi_{b}=0.6 \mathrm{~V}, a=0.8 \mu \mathrm{~m}, Z / L=50, \mu_{e}=1500 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}$, and $N_{D n}=5 \times 10^{15} \mathrm{~cm}^{-3}$.

This condition is called saturation. In this region the drain current remains fixed (i.e., saturated) at its value just prior to pinchoff of the channel. We call this current the saturation value $i_{D, \text { sat }}$. Putting $v_{D S}=v_{G S}-V_{P}$ into Eq. (10.61) for $i_{D}$, we obtain

$$
\begin{align*}
i_{D, \text { sat }}= & a \frac{Z}{L} q \mu_{e} N_{D n}\left\{\left(v_{G S}-V_{P}\right)-\frac{2}{3} \sqrt{\frac{2 \varepsilon_{\mathrm{Si}}}{q N_{D n} a^{2}}}\right. \\
& \left.\times\left[\left(\phi_{b}-V_{P}\right)^{3 / 2}-\left(\phi_{b}-v_{G S}\right)^{3 / 2}\right]\right\} \tag{10.65}
\end{align*}
$$

This equation is plotted along with Eq. (10.61) in Fig. 10.22 for the same device as in Fig. 10.21.

This completes the gradual channel model for the JFET. To summarize our model, when $v_{B S} \leq 0, v_{D S} \geq 0$, and $v_{G S} \leq V_{O N}$; the substrate and gate currents, $i_{B}$ and $i_{G}$, are zero. The drain current $i_{D}$ is also zero if $v_{G S} \leq V_{P}$. In this case, which we can also write as ( $v_{G S}-V_{P}$ ) $\leq 0$, the device is said to be in pinchoff. If $0 \leq\left(v_{G S}-V_{P}\right)$, then $i_{D}$ is given by Eq. (10.61) when $0 \leq v_{D S} \leq\left(v_{G S}-V_{P}\right)$ and by Eq. (10.65) when $0 \leq\left(v_{G S}-V_{P}\right) \leq v_{D S}$. The latter range of $v_{D S}$ is called the saturation region, and the former is termed the linear region.

The drain current expressions are complicated in appearance, and it is difficult to do much about simplifying them in a meaningful way. One modification of their presentation is to use the definition for $V_{P}$ [Eq. (10.62)] to simplify the factor $\left(2 \varepsilon_{\mathrm{Si}} / q N_{D n} a^{2}\right)^{1 / 2}$ and to replace the factor $q \mu_{e} N_{D n}$ with the channel conductivity $\sigma_{o}$. Going further, we can define $G_{o}$ as the conductance of the undepleted channel.


FIGURE 10.22
Plot from Fig. 10.21 extended into the saturation and pinchoff regions.
Using the same device parameters as in Fig. 10.21, we obtain $V_{p}=-2$
V and $G_{o}=4.8 \mathrm{mS}$.

$$
\begin{equation*}
G_{o} \equiv a \frac{Z}{L} q \mu_{e} N_{D n}=\sigma_{o} a \frac{Z}{L} \tag{10.66}
\end{equation*}
$$

and then write

$$
\begin{equation*}
i_{D}=G_{o}\left\{v_{D S}-\frac{2}{3}\left[\frac{\left(\phi_{b}-v_{G S}+v_{D S}\right)^{3 / 2}-\left(\phi_{b}-v_{G S}\right)^{3 / 2}}{\left(\phi_{b}-V_{P}\right)^{1 / 2}}\right]\right\} \tag{10.67}
\end{equation*}
$$

when $0 \leq v_{D S} \leq\left(v_{G S}-V_{P}\right)$, and

$$
\begin{equation*}
i_{D}=i_{D, \text { sat }}=G_{o}\left\{\left(v_{G S}-V_{P}\right)-\frac{2}{3}\left[\frac{\left(\phi_{b}-V_{P}\right)^{3 / 2}-\left(\phi_{b}-v_{G S}\right)^{3 / 2}}{\left(\phi_{b}-V_{P}\right)^{1 / 2}}\right]\right\} \tag{10.68}
\end{equation*}
$$

when $0 \leq\left(v_{G S}-V_{P}\right) \leq v_{D S}$.

## Example

The characteristics in Figs. 10.21 and 10.22 have been plotted for a device with typical dimensions and doping levels. As stated in the captions for these figures, the characteristics correspond to a silicon device with $\phi_{b}=0.6 \mathrm{~V}, a=0.8 \mu \mathrm{~m}$, $Z / L=50, \mu_{e}=1500 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}$, and $N_{D n}=5 \times 10^{15} \mathrm{~cm}^{-3}$; and thus for which $V_{p}=-2 \mathrm{~V}$ and $G_{o}=4.8 \mathrm{mS}$.

As was the case with MOSFETs, there are also several types of JFETs. We have just developed a model for an $n$-channel JFET; there are also $p$-channel JFETs, which are modeled in the same way with identical results except, as
you might expect, that all of the voltages and currents change sign. Also, the implication in our modeling discussion was that the channel was not pinched off when no voltage was applied to the gate. In terms of $V_{P}$, the implication was that the pinchoff voltage for an $n$-channel device was negative (i.e., $V_{P}<0$ ). When this is the case, the device is said to be a depletion mode JFET. If $V_{P}$ for an $n$-channel device is positive (i.e., $V_{P} \geq 0$ ), there will be no channel until the gate junction is forward-biased. Such a device is called an enhancement mode JFET. Clearly there is a limit to how far forward the gate junction of a JFET can be biased before it conducts heavily, so there is a limit to how strongly an enhancement mode JFET can be turned on. For this reason, enhancement mode JFETs are much less common than depletion mode JFETs. The circuit schematic symbols used for $n$ - and $p$-channel JFETs are illustrated in Fig. 10.23.

### 10.2.2 Static Small-Signal Linear Model

The static small-signal linear model for the JFET is topologically the same as that for the MOSFET, which was illustrated in Fig. 10.13. The definitions for all of the parameters, $g_{m}, g_{m b}$, and $g_{o}$, are also identical and are given by Eqs. (10.38), (10.39), and (10.40). What is different is that we must use the JFET equations to evaluate these definitions. We will examine each in turn.

The forward transconductance $g_{m}$ is found to have the following forms in the various operating regions:

$$
g_{m}= \begin{cases}0 & \text { for }\left(V_{G S}-V_{P}\right) \leq 0 \leq V_{D S}  \tag{10.69}\\ G_{o} \frac{\sqrt{\phi_{b}-V_{P}}-\sqrt{\phi_{b}-V_{G S}}}{\sqrt{\phi_{b}-V_{P}}} & \text { for } 0 \leq\left(V_{G S}-V_{P}\right) \leq V_{D S} \\ G_{o} \frac{\sqrt{\phi_{b}-V_{G S}+V_{D S}}-\sqrt{\phi_{b}-V_{G S}}}{\sqrt{\phi_{b}-V_{P}}} & \text { for } 0 \leq V_{D S} \leq\left(V_{G S}-V_{P}\right)\end{cases}
$$



(b)

FIGURE 10.23
Symbols used for $n$ - and $p$-channel JFETs in circuit schematic drawings: (a) $n$-channel JFET; (b) p-channel JFET.

Notice that $g_{m}$ has its maximum values in saturation. Looking a bit more closely at $g_{m}$ in saturation, Eq. (10.70), we see that we can also write this equation as

$$
g_{m}=G_{o}\left[1-\sqrt{\frac{\left(\phi_{b}-V_{G S}\right)}{\left(\phi_{b}-V_{p}\right)}}\right]
$$

Written this way it is easy to see that $g_{m}$ is a maximum when the gate junction is as forward-biased as possible, usually on the order of 0.3 or 0.4 V , and that $G_{o}$ is a firm upper bound on $g_{m}$. It might seem desirable to make $V_{p}$ as negative as possible to make the denominator of the fraction small, but this is usually not a wise design choice. A large $V_{p}$ requires a large $V_{D S}$ to put the device in saturation, and this leads to large power dissipation. We usually want to keep $V_{p}$ on the order of a volt or two.

The substrate transconductance $g_{m b}$ is zero in our model because we have said that the depletion region on the $n$-side of the lower $p-n$ junction is negligible. We can thus eliminate the $g_{m b} v_{b s}$ current source from the small-signal incremental model and simplify it to that shown in Fig. 10.24.

Finally, the output conductance $g_{0}$ is given by the following expressions in the various regions of operation:

$$
g_{o}= \begin{cases}0 & \text { for }\left(V_{G S}-V_{P}\right) \leq 0 \leq V_{D S}  \tag{10.72}\\ 0 & \text { for } 0 \leq\left(V_{G S}-V_{P}\right) \leq V_{D S} \\ G_{0}\left[1-\sqrt{\frac{\left(\phi_{b}-V_{G S}-V_{D S}\right)}{\left(\phi_{b}-V_{P}\right)}}\right] & \text { for } 0 \leq V_{D S} \leq\left(V_{G S}-V_{P}\right)\end{cases}
$$

## Example

Question. Consider a device with the output characteristics shown in Fig. 10.22. What is the small-signal transconductance $g_{m}$ of this device if it is biased in saturation with $\nu_{G S}=0 \mathrm{~V}$ ?

Discussion. Using the fact that for this structure $\phi_{b}=0.6 \mathrm{~V}, V_{P}=-2 \mathrm{~V}$, and $G_{o}=4.8 \mathrm{mS}$, we find using Eq. ( $10.70^{\prime}$ ) that $g_{m}$ is 2.5 mS , or about half the value of $G_{o}$. By forward-biasing the gate $0.4 \mathrm{~V}, g_{m}$ can be increased to 3.5 mS . Looking at Fig. 10.22, we see that the drain current values would be approximately 2.4 mA and 3.7 mA , respectively, at these two bias points. Clearly, JFETs, like MOSFETs, have relatively low transconductances in comparison to bipolar transistors.

The model of Fig. 10.24 is valid for both $n$ - and $p$-channel JFETs, but the expressions in Eqs. (10.69) through (10.74) were derived for an $n$-channel device. To modify them for a $p$-channel device we must write absolute value signs around all of the factors under the square root signs [e.g., $\left(\phi_{b}-V_{P}\right)^{1 / 2}$ ] and the various bias ranges must be defined properly. That is, for a $p$-channel device, cutoff corresponds to $V_{D S} \leq 0 \leq\left(V_{G S}-V_{P}\right)$; the saturation region corresponds to $V_{D S} \leq\left(V_{G S}-V_{P}\right) \leq 0$; and the linear region corresponds to $\left(V_{G S}-V_{P}\right) \leq V_{D S} \leq 0$.


FIGURE 10.24
Linear small-signal equivalent circuit of a JFET biased in its forward operating region.

### 10.2.3 High-Frequency Small-Signal Model

The common-source small-signal high-frequency equivalent circuit for a JFET is the same as that of a MOSFET shown in Fig. 10.18 with $g_{m b}=0$. We must retain the substrate terminal in this model because $\nu_{b s}$ is not necessarily zero, although it often is, and current may flow through the capacitors $C_{s b}$ and $C_{d b}$.

### 10.3 METAL-SEMICONDUCTOR FIELD EFFECT TRANSISTORS

The final field effect transistor that we will study in this text is the metalsemiconductor field effect transistor, or MESFET. This device is very similar to a JFET, as we shall see in the next subsection, and we have already done much of its basic analysis. However, because MESFETs can be made with extremely short gate lengths and because they are typically fabricated of very high-mobility semiconductors, we must be very careful to include velocity saturation. We will do this in the final subsection after first introducing the basic MESFET structure and model.

### 10.3.1 Basic Concept and Modeling

In Chap. 6, when we first discussed making electrical contact to a semiconductor, we pointed out that there is a difference in electrostatic potential between a metal and a semiconductor. We also said that there in general will be a depletion region in the semiconductor adjacent to the metal-semiconductor interface. When forming electrical contacts, our objective is to make the depletion region at this interface as thin as possible and the barrier as low as possible (by heavily doping the semiconductor and by choosing a metal that yields a low barrier) so that this barrier does not form an impediment to current flow. In other situations, however, we can go the other way. If the semiconductor is lightly doped and the barrier is high, there will be a wide depletion region and an appreciable barrier for current flow. The metal-semiconductor interface will then behave very much like a $p^{+}$$n$ or $p-n^{+}$junction diode, where the metal plays the role of the heavily doped semiconductor. Such structures are called metal-semiconductor diodes or Schottky diodes.

Schottky diodes have a number of important features and applications, many of which are discussed in App. E. For our present discussion, we want to exploit the fact that the semiconductor is depleted adjacent to the metal and that, as in a $p-n$ diode, the width of this depletion region increases with increasing reverse bias on the diode. This situation is illustrated in Fig. 10.25 for a Schottky diode on $n$-type silicon. The device and the electrostatic potential and net charge profiles through it are shown for zero and reverse bias. As in an abrupt $p^{+}-n$ junction, the change in electrostatic potential occurs entirely across the depletion region of


FIGURE 10.25
(a) Structure of a metal-semiconductor diode; (b) the corresponding electrostatic potential distribution; (c) the net charge distribution. (The solid line represents zero bias, and the dashed line represents an applied reverse bias $V_{M S}<0$.)
the $n$-type material. It is given by

$$
\begin{equation*}
x_{D} \approx \sqrt{\frac{2 \varepsilon_{S_{i}}\left(\phi_{b}-v_{M S}\right)}{q N_{D n}}} \tag{10.75}
\end{equation*}
$$

where $N_{D n}$ is the doping level in the semiconductor and $\phi_{b}$ is the built-in potential of the Schottky diode.

A Schottky diode like this can be used in place of the p-n junction in the gate of a JFET, as shown in Fig. 10.26. The resulting device is called either a Schottky-gate field effect transistor or, more commonly, a metal-semiconductor field effect transistor (MESFET). Except for the difference in the barrier height, this device is electrically identical to the JFET, certainly for purposes of the largeand small-signal modeling we have done; as such, we already have models for it.

As a practical matter, the MESFET has certain important advantages over the JFET and is a much more widely used device. It is very easy to fabricate and is particularly attractive for use on semiconductors other than silicon (e,g., gallium arsenide) in which it is technologically more difficult, inconvenient, or even impossible to make good $p-n$ junctions. It can also be made very small, so devices with very short channels (i.e., small $L$ ) can easily be made in order to get very fast devices. The major disadvantage of the MESFET in some material systems is that it is difficult to find metals that yield sufficiently high barriers; thus in these situations the gate junction is too conductive when reverse-biased (and so is termed "leaky"). In general, however, MESFETs have been very successfully used with many semiconductors, and they are widely used in high-speed applications.

### 10.3.2 Velocity Saturation in MESFETs

In developing our large-signal FET models we have assumed that the velocity of the carriers in the channel can be written as the product of their mobility and the electric field. At the same time, however, we know from our discussion in


FIGURE 10.26
Cross-sectional drawing of a typical $n$-channel metal-semiconductor field effect transistor.

Chap. 3 that the assumption of a linear relationship between velocity and field is not valid at high fields. This is traditionally not a problem in silicon devices because velocity saturation does not occur in silicon until the electric field is well in excess of $10 \mathrm{kV} / \mathrm{cm}$; if the gate length is 1 to $2 \mu \mathrm{~m}$, this field is only reached for drain-to-source voltages of several volts, where the MOSFET is typically entering saturation anyway. In such a situation, accounting for velocity saturation has little impact on the characteristics.* For the semiconductors commonly used to make MESFETs, however, velocity saturation can occur at $3 \mathrm{kV} / \mathrm{cm}$ or less. This fact, coupled with the fact that gate lengths $L$ in MESFETs can be as small as $0.25 \mu \mathrm{~m}$ or less, means that the critical field strength for velocity saturation in these devices can be exceeded at drain-to-source voltages of less than 0.1 V . Consequently, our assumption of a constant mobility is not valid over much of the normal operating range of these devices, so our model must be modified.

The starting point for our new model is the same as it was before, that is, Eq. (10.59), which relates the current in the channel to the product of the carrier concentration and the carriers' velocity, except that now instead of writing the velocity as $\mu_{e} \mathscr{C}_{y}$, we write it as $s_{y}\left(\mathscr{C}_{y}\right)$ :

$$
\begin{equation*}
i_{D}=Z q N_{D n}\left[a-x_{D}(y)\right] s_{y}\left[\mathscr{E}_{y}(y)\right] \tag{10.76a}
\end{equation*}
$$

where $x_{D}(y)$ is now given by Eq. (10.75) with $v_{M S}$ replaced with [ $v_{G S}-v_{C S}(y)$ ]. The velocity $s_{y}$ is a function of $y$ because the electric field $\mathscr{E}_{y}$ is a function of $y$; the electric field is, as before, $-d v_{C S} /\left.d y\right|_{y}$. Thus

$$
\begin{equation*}
i_{D}=Z q N_{D n}\left\{a-\sqrt{\frac{2 \varepsilon_{S \mathrm{i}}\left[\phi_{b}-v_{G S}+v_{C S}(y)\right]}{q N_{D n}}}\right\} s_{y}\left[\mathscr{E}_{y}(y)\right] \tag{10.76b}
\end{equation*}
$$

or

$$
\begin{equation*}
i_{D}=Z q N_{D n} a\left[1-\sqrt{\frac{\phi_{b}-v_{G S}+v_{C S}(y)}{\phi_{b}-V_{P}}}\right] s_{y}[\mathscr{E} y(y)] \tag{10.76c}
\end{equation*}
$$

with $V_{P}$ defined in Eq. (10.62).
The key issue now is how to model the velocity-field relationship, which was shown in Fig. 3.2. We will consider two models that have been widely applied; both are illustrated in Fig. 10.27. The simplest way to model the velocity-field curve is to use a two-segment piecewise linear approximation:

$$
s_{y}\left[\mathscr{E}_{y}(y)\right]= \begin{cases}\mu_{e} \mathscr{E}_{y} & \text { for } \mathscr{E}_{y} \leq \mathscr{E}_{\text {crit }}  \tag{10.77}\\ \mu_{e} \mathscr{E}_{\text {crit }} \equiv s_{\text {sat }} & \text { for } \mathscr{E}_{\text {crit }} \leq \mathscr{E}_{y}\end{cases}
$$

where $\mu_{e}$ is the low-field mobility and $\mathscr{E}_{\text {crit }}$ is the field at which the velocity saturates. A function like this is convenient for hand calculations but is more

[^9]

FIGURE 10.27
Plot of the two models given in Eqs. (10.77) and (10.78) for the velocity-field relationship of a typical semiconductor.
difficult to use with computer simulation, so a second commonly used model is one that fits a single analytical expression to the entire curve:

$$
\begin{equation*}
s_{y}\left[\mathscr{E}_{y}(y)\right]=\frac{\mu_{e} \mathscr{E}_{y}}{\left(1+\mathscr{E}_{y} / \mathscr{E}_{\text {crit }}\right)} \tag{10.78}
\end{equation*}
$$

We used this model for velocity saturation in MOSFETs (Sec. 10.1.1c).
In both models $s_{y}$ is $\mu_{e} \mathscr{E}_{y}$ when $\mathscr{E}_{y}$ is much less than $\mathscr{E}_{\text {crit }}$ and is $\mu_{e} \mathscr{E}_{\text {crit }}$ (which we define as $s_{\text {sat }}$ ) for $\mathscr{E}_{y}$ much greater than $\mathscr{E}_{\text {crit }}$. In between, the models are clearly quite different, yet both retain the essentials of velocity saturation. In treating the MESFET, we will use the piecewise linear model because it better matches the sharp saturation characteristics of high-mobility compound semiconductors. This model is also convenient to use because as long as the field in the channel is less than $\mathscr{E}_{\text {crit }}$, it is the same as our original model. Once the field exceeds $\mathscr{E}_{\text {crit }}$, the carrier velocity (and therefore the current) saturates, just as it does above pinchoff in the gradual channel approximation. However, now the critical drain-to-source voltage for the onset of saturation occurs not when the channel at the drain end becomes pinched off, but rather when the carriers at the drain end of the channel reach their saturation velocity. Referring to Eq. (10.76b), we can see that the saturation current $i_{D, \text { sat }}$ and drain-to-source voltage $\nu_{D S, \text { sat }}$ must be related as

$$
\begin{equation*}
i_{D, \text { sat }}=Z q N_{D n}\left[a-\sqrt{\frac{2 \varepsilon_{S i}\left(\phi_{b}-v_{G S}+v_{D S, \text { sat }}\right)}{q N_{D n}}}\right] s_{\mathrm{sat}} \tag{10.79a}
\end{equation*}
$$

Using our earlier definitions of $G_{0}$ [Eq. (10.66)] and $V_{P}$ [Eq. (10.62)], this can be written as

$$
\begin{equation*}
i_{D, \mathrm{sat}}=G_{o}\left[1-\frac{\left(\phi_{b}-v_{G S}+v_{D S, \mathrm{sat}}\right)^{1 / 2}}{\left(\phi_{b}-V_{P}\right)^{1 / 2}}\right] \frac{s_{\mathrm{sat}} L}{\mu_{e}} \tag{10.79b}
\end{equation*}
$$

The values of $i_{D, \text { sat }}$ and $v_{D S, \text { sat }}$ must also satisfy the $i_{D}\left(v_{G S}, v_{D S}\right)$ expression in the linear region, Eq. (10.67):

$$
\begin{equation*}
i_{D, \text { sat }}=G_{o}\left\{v_{D S, \text { sat }}-\frac{2}{3}\left(\frac{\left[\left(\phi_{b}-v_{G S}+v_{D S, \text { sat }}\right)^{3 / 2}-\left(\phi_{b}-v_{G S}\right)^{3 / 2}\right]}{\left(\phi_{b}-V_{P}\right)^{1 / 2}}\right)\right\} \tag{10.80}
\end{equation*}
$$

The values of $i_{D, \text { sat }}$ and $v_{D S, \text { sat }}$ that we seek must be the common solution of these two equations. A convenient way to find this solution is graphically, which we illustrate in Fig. 10.28 for a GaAs MESFET, with the dimensions and parameters indicated in the caption. For comparison the dashed curve shows what the characteristics would be without velocity saturation. Several interesting differences are apparent. First, the saturation current is reduced substantially, which is not good. At the same time, however, the saturation occurs at a lower voltage and the curves are crisper, which is good. Since we cannot do much about the former difference, we might as well appreciate the latter.

It is difficult with only a graphical solution to get much design insight from this model and to see, for example, what we can do to modify $i_{D, \text { sat }}$ and $v_{D S, \text { sat }}$. To get a more analytical model, we next notice in Fig. 10.28 that velocity saturation occurs while the device is still well within the classical linear region (i.e., where the depletion region width changes very little along the length of the channel).


FIGURE 10.28
Output characteristics of a GaAs MESFET with $\phi_{b}=0.9 \mathrm{~V}$, $a=0.15 \mu \mathrm{~m}, Z / L=50, L=0.5 \mu \mathrm{~m}, \mu_{e}=2500 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}, s_{\text {sat }}=$ $10^{7} \mathrm{~cm} / \mathrm{s}$, and $N_{D n}=6.7 \times 10^{16} \mathrm{~cm}^{-3}$. The piecewise linear model of Eq. (10.77) is used for the velocity-field curve, and saturation is determined from the graphical solution of Eqs. (10.79) and (10.80).

Here the current is given approximately by the resistance of the channel times the drain-to-source voltage, that is,

$$
\begin{equation*}
i_{D} \approx q \mu_{e} N_{D n} \frac{Z}{L}\left[a-x_{D_{o}}\right] v_{D S} \tag{10.81}
\end{equation*}
$$

where

$$
\begin{equation*}
x_{D_{o}} \equiv \sqrt{\frac{2 \varepsilon_{S i}\left(\phi_{b}-v_{G S}\right)}{q N_{D n}}} \tag{10.82}
\end{equation*}
$$

This will be valid until $v_{D S} / L=\mathscr{E}_{\text {crit }}$, at which point the velocity saturates at $s_{\text {sat }}$ and $i_{D}$ saturates at

$$
\begin{equation*}
i_{D, \text { sat }}=q N_{D n} Z\left(a-x_{D_{0}}\right) s_{\text {sat }} \tag{10.83}
\end{equation*}
$$

This last result shows us the importance of choosing a material with a large $s_{\text {sat }}$, along with a large $\mu_{e}$ and small $\mathscr{E}_{\text {crit }}$.

To compare the results of this model with our earlier models, it is convenient to write Eqs. (10.81) and (10.83) in terms of $a$ and $V_{P}$ using Eqs. (10.62) and (10.66). We find that we can then summarize our results as follows:

$$
i_{D}= \begin{cases}G_{0}\left[1-\frac{\left(\phi_{b}-v_{G S}\right)^{1 / 2}}{\left(\phi_{b}-V_{P}\right)^{1 / 2}}\right] v_{D S} & \text { for } v_{D S} \leq \mathscr{E}_{\text {crit }} L \text { and } v_{G S} \geq V_{P}  \tag{10.84}\\ G_{0}\left[1-\frac{\left(\phi_{b}-v_{G S}\right)^{1 / 2}}{\left(\phi_{b}-V_{P}\right)^{1 / 2}}\right] \frac{s_{\text {sat }} L}{\mu_{e}} & \text { for } \mathscr{E}_{c r i t} L \leq v_{D S} \text { and } v_{G S} \geq V_{P} \\ 0 & \text { for } v_{G S} \leq V_{P}\end{cases}
$$

These expressions are plotted in Fig. 10.29 for the same device used in Fig. 10.28. In Fig. 10.29a, $i_{D} / G_{o}$ is plotted, just as in Fig. 10.28. In Fig. 10.29b, $i_{D}$ is plotted and $G_{o}$ has been adjusted to yield the same peak current as when $\nu_{G S}$ is 0.5 V . We adjust $G_{o}$ [see Eq. (10.66)] by, for example, changing the value used for $\mu_{e}$ or the product $a N_{D n}$ to get a proper fit. If we do the latter, the values of $a$ and $N_{D n}$ must then also be adjusted so that the product $a^{2} N_{D n}$ is unchanged in order to ensure that $V_{P}$ will remain the same. In the present case, this means that to obtain the solid curves in Fig. $10.29 b$ we had to assume that $a$ is 0.2 mm and $N_{D_{n}}$ is $5 \times 10^{16} \mathrm{~cm}^{-3}$.

This relatively simple model is seen to give very similar results to our earlier model, but we can now see several additional features. First, we see that the saturation voltage $v_{D S}$ sat is independent of $v_{G S}$ and $i_{D, \text { sat }}$, whereas when velocity saturation is not an issue it increases parabolically with $i_{D, \text { sat }}$. Second, since in this approximation $v_{D S}$, sat is $\mathscr{E}_{\text {crit }} L$, to make $v_{D S \text {, sat }}$ small we need a short channel and low critical field. Third, we see that $i_{D, \text { sat }}$ is $K s_{\text {sat }}$, so to make $v_{D S, \text { sat }}$ large we want $s_{\text {sat }}$ and $K$ large. The latter is made large by using a wide device, by making the product $N_{D n} a$ as large as possible while still obtaining the desired $V_{P}$, and by keeping the gate leakage within acceptable bounds (which means that $N_{D n}$ cannot be too large). Finally, we note that the spacing of the constant $v_{G S}$


FIGURE 10.29
Output characteristics for the same MESFET as in Fig. 10.28, calculated using the approximation summarized in Eqs. 10.84: (a) plot of ( $i_{D} / G_{o}$ ) versus $v_{D S}$ (the dashed curves represent the solid curves in Fig. 10.28); (b) plot of $i_{D}$ versus $v_{D S}$ for $G_{o}$ adjusted to yield the same peak current as when $v_{G S}$ is 0.5 V .
curves is, in general, more uniform when velocity saturation is a factor. (Compare the solid and dashed curves in Fig. 10.28, for example.) Even after adjusting $G_{o}$ to match the curves for $v_{G S}=0.5 \mathrm{~V}$, the values of $i_{D, \text { sat }}$ still differ in the two models, but this difference is larger as $\nu_{G S}$ approaches $V_{P}$. If we were to add curves for $v_{G S}$ equal to 0.7 V and/or 0.8 V , for example, we would find closer agreement in those curves.

Before leaving velocity saturation, we should point out that we can also find an analytical expression for $i_{D}\left(v_{G S}, v_{D S}\right)$ by using the second velocity-field
model we introduced, Eq. (10.78). To do this, we substitute Eq. (10.78) for $s_{y}$ into Eq. (10.76b) for $i_{D}$, solve for $\mathscr{E}_{y}$, replace $\mathscr{E}_{y}$ with $-d v_{C S} / d y$, and integrate from source to drain. We have chosen not to go through this exercise because the algebra is tedious and teaches us little, but you should realize that it is possible.

### 10.4 SUMMARY

In this chapter we have considered a second class of transistors, field effect transistors (FETs). These devices differ from bipolar junction transistors (BJTs) in that the potential barrier to current flow through the device is controlled indirectly by a field plate called the gate, rather than by direct contact to the barrier region. They also differ in that the output current is due to majority carrier drift in the channel, rather than due to minority carrier diffusion across the base. There are both $n$ - and $p$-channel FETs, differing in the majority carrier type in the channel.

We have introduced three types of field effect transistors: the metal-oxidesemiconductor FET (MOSFET), the junction-gate FET (JFET), and the metalsemiconductor FET (MESFET). All have a characteristic gate voltage below which the channel does not conduct and the device is cut off; but with sufficient gate voltage the channel conducts and the device is either in the linear, or triode, region, which occurs at low output voltages, or is saturated, which occurs at larger output voltages and corresponds to a constant output, or drain, current independent of the drain-to-source voltage. If the channel is conducting when the gate voltage is zero, the device is said to be a depletion mode device; if it is not, the device is termed an enhancement mode device. We have used the gradual channel approximation model to describe the large-signal terminal characteristics of FETs. From the results of that modeling we have also obtained linear smallsignal models. We have seen that an important characteristic of FETs is their very high input impedance.

## PROBLEMS

10.1 Consider an $n$-channel MOSFET with $t_{0}=50 \mathrm{~nm}, \varepsilon_{0}=3 \times 10^{-13} \mathrm{f} / \mathrm{cm}^{2}, L=$ $1 \mu \mathrm{~m}$, and $\mu_{e}=1200 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}$. Assume a bias level $\left(V_{G S}-V_{T}\right)=2 \mathrm{~V}$ and $v_{D S}>2 \mathrm{~V}$.
(a) If we want $I_{D}$ to be 1 mA for this bias condition, what must $K$ be for this device? Recall that $i_{D}=K\left(v_{G S}-V_{T}\right)^{2} / 2$ when $v_{D S}>\left(v_{G S}-V_{T}\right)$.
(b) What must $W$ be for the device with the value of $K$ you found in part a?
(c) What is the incremental transconductance $g_{m}$ of this device at this bias point? Compare this to $g_{m}$ of a bipolar transistor with $I_{C}=1 \mathrm{~mA}$.
(d) Consider designing a MOSFET with $g_{m}=40 \mathrm{mS}$ at a bias level $I_{D}=1 \mathrm{~mA}$.
(i) What $K$ value is required?
(ii) To achieve this $K$ in the MOSFET structure described above, what $W$ is required?
(iii) With this $K$, what is $\left(V_{G S}-V_{T}\right)$ when $I_{D}=1 \mathrm{~mA}$ ? Compare this result to $k T$ and discuss.
10.2 Consider an $n$-channel silicon MOSFET like that pictured in Fig. 10.2 that has the following dimensions and properties:

$$
\begin{aligned}
t_{o} & =750 \AA \\
N_{A} & =1 \times 10^{16} \mathrm{~cm}^{-3} \\
V_{\mathrm{FB}} & =-0.2 \mathrm{~V} \\
\mu_{e} & =800 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{~s} \\
L & =2 \mu \mathrm{~m} \\
W & =30 \mu \mathrm{~m}
\end{aligned}
$$

(a) What is the threshold voltage $V_{T}$ of this device when $v_{B S}=0$ ?
(b) What is the value of the factor $K$ in the large-signal model for $i_{D}\left(v_{G S}, v_{D S}, v_{B S}\right)$ [see Eqs. (10.15)]?
(c) What is $i_{D}$ when $v_{G S}=+2 \mathrm{~V}, v_{D S}=+5 \mathrm{~V}$, and $v_{B S}=0$ ?
10.3 Consider a $p$-channel enhancement mode MOSFET with $V_{T}=-1 \mathrm{~V}$ and $K=$ $2 \mathrm{~mA} / \mathrm{V}^{2}$ connected as a diode as illustrated in Fig. P10.3.
(a) Calculate and graph $i_{D}$ as a function of $v_{D S}$ for $-5 \mathrm{~V} \leq v_{D S} \leq 5 \mathrm{~V}$.
(b) Based on your results in part a, suggest a method of plotting $i_{D}$ versus $v_{D S}$ for such a connection that will yield (theoretically, at least) two straight lines intersecting at $V_{T}$.
(c) Suppose that the base and source terminals are now disconnected and that a positive supply $V_{B S}$ is inserted. How would your plot in part a change qualitatively as $\left|V_{B S}\right|$ is increased?
10.4 Using the same design rules as in problem 8.9 , lay out minimum-gate-length MOSFETs like those pictured in Figs. $10.11 a$ and $b$. Assume that $W$ is $10 \mu \mathrm{~m}$. Compare the sizes of these two devices, especially the gate lengths $L$. Discuss the relative sizes of the gate-to-drain capacitance $C_{g d}$ due to the overlap of the gate electrode and the drain diffusion in your two designs. Do the same comparison of your two designs with respect to the drain-to-substrate capacitance $C_{d b}$, which arises from the depletion capacitance of the drain diffusion.
10.5 Suppose that you are an engineer with a company that has a MOSFET processing facility that can reliably produce features with dimensions as small as $1.5 \mu \mathrm{~m}$ and can reliably produce gate oxides as thin as $20 \mathrm{~nm}(200 \AA)$. The process uses


FIGURE P10.3
polycrystalline silicon doped with the same carrier type as the source and drain for the gate "metal"; the doping level of this gate material is typically $10^{19} \mathrm{~cm}^{-3}$. The electron mobility in the channel is $500 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}$; the hole mobility is $150 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}$.

Using these capabilities, specify $W, L, t_{o}$, and $N_{A p}$ for an $n$-channel enhancement mode MOSFET to obtain the following characteristics:

$$
\begin{aligned}
& \text { Threshold voltage : } V_{T}=0.5 \\
& \qquad K \text {-factor : } \frac{W}{L} \mu_{e} \frac{\varepsilon_{o}}{t_{o}}=2 \mathrm{~mA} / \mathrm{V}^{2}
\end{aligned}
$$

Find the minimum gate capacitance possible given the above constraints.
10.6 You should have found that $V_{T}$ for the device in problem 10.2 was such that the device is an enhancement mode FET. Often we want to selectively convert some of the FETs in an integrated circuit from enhancement mode to depletion mode. This is done by using a process called ion implantation to put positive or negative ions at the semiconductor oxide interface, which effectively changes $Q_{I}$ and thereby $V_{\mathrm{FB}}$. [See Sec. 9.5 and Eq. (9.33).] Suppose that you want to make the threshold of devices like this -2 V .
(a) How much does the flat-band voltage have to be changed, and what must its new value be?
(b) Does the charge introduced need to be positive or negative?
(c) What sheet density of ions (number of ions $/ \mathrm{cm}^{2}$ ) has to be introduced? (Assume that the ions are singly ionized.)
10.7 Calculate the body effect coefficient $\eta$ [see Eq. (10.50)] for
(a) The MOSFET in problem 10.2
(b) The MOSFET you designed in problem 10.5
10.8 This problem concerns velocity saturation in MOSFETs.
(a) Assume a piecewise linear velocity field model as in Eq. (10.77). Using this model along with Eq.(10.4a) and the approximation for the channel charge in Eq. ( $10.5^{\prime}$ ), find a relationship for $i_{D, \text { sat }}$ and $v_{D S \text {,sat }}$ that is the MOSFET analog of Eq. (10.79) for a MESFET. Equation (10.10) is a second relationship satisfied by $i_{D, \text { sat }}$ and $v_{D S, \text { sat }}$, so with these two relationships unique values may be found for $i_{D, \text { sat }}$ and $v_{D S, \text { sat }}$ for each value of $v_{G S}$.
(b) The critical field for velocity saturation in silicon is $2 \times 10^{4} \mathrm{~V} / \mathrm{cm}$. Assuming for purposes of estimation that the field in the channel is uniform (i.e., that $\left.\mathscr{E}=v_{D S} / L\right)$, at what $v_{D S}$ will the field be $2 \times 10^{4} \mathrm{~V} / \mathrm{cm}$ in devices with the following channel lengths?
(i) $1.0 \mu \mathrm{~m}$
(ii) $0.25 \mu \mathrm{~m}$
(iii) $0.1 \mu \mathrm{~m}$
10.9 Redesign the channel height $a$ and doping level $N_{D n}$ of the device in the example in Sec. 10.2 .1 to achieve the same $G_{o}$ but a pinchoff voltage $V_{p}$ of -1.2 V . The same mask set is to be used to fabricate the device, so $Z / L$ is unchanged.
10.10 (a) Calculate the small-signal transconductance $g_{m}$ in saturation for the MESFET model incorporating velocity saturation summarized by Eq. (10.84) and com-
pare your expression to that found when velocity saturation is not a factor, Eq. (10.70).
(b) Evaluate $g_{m}$ using each of your expressions in part a for the device used in Fig. 10.28 and at the same $v_{G S}$ values used in that figure (i.e., $-0.3,-0.1$, $0.1,0.3$, and 0.5 V ).
10.11 Plot $i_{D}$ versus $v_{D S}$ curves for a gate-to-source voltage $v_{G S}$ of 0.7 V like those in Figs. 10.28 and $10.29 b$. Note that you should plot $i_{D}$, not $i_{D} / G_{O}$.

## CHAPTER 11

## SINGLETRANSISTOR LINEAR AMPLIFIER STAGES

We now have models for bipolar and field effect transistors, and we understand how those models are based upon and related to the physical processes active within their respective devices. Next we will turn to applying transistors in useful circuits and to using our models to analyze, understand, and eventually design transistor circuits.

Transistor circuits can be divided into several groups; for each group a different type of analysis is appropriate. In Chaps. 11 through 14 we will consider transistor circuits designed to linearly multiply time-varying input signals by a constant factor, usually of magnitude much greater than 1 . Such circuits are called linear amplifiers. The circuits we will discuss are designed so that the transistors in them are always biased in their forward active regions and can always be modeled using small-signal linear equivalent circuit models. These circuits are called Class A amplifiers and are what we will mean when we speak of "small-signal linear amplifiers."

Linear amplifier circuits can also be designed in which some of the transistors operate outside of their forward active regions and for which large-signal models must be used for some of the devices. We will not discuss these amplifiers, called Class $B$ and Class $C$ amplifiers, in any detail in this text.

Finally, there is a third group of transistor circuits that are highly nonlinear and for which large-signal models are used exclusively. These are switching circuits for use in digital logic, semiconductor memories, and various signal processing applications. We will discuss this group of circuits more in Chap. 15.

In this chapter we will begin with the all-important issue of establishing a stable bias point for a transistor. Then we will study simple circuits, each with a
single transistor, that can be used as building blocks to assemble more complicated linear amplifier circuits. In Chap. 12, we will discuss additional linear amplifier building block circuits that use transistor pairs, and in Chap. 13 we will discuss assembling these building block circuits into complex multistage linear amplifiers.

### 11.1 BIASING TRANSISTORS

Our small-signal linear equivalent circuit models depend critically on the transistor bias point, so a major issue in designing a transistor amplifier is establishing a bias point in the forward active region for each of the transistors. Furthermore, because the transconductance $g_{m}$ is in general the most important of the equivalent circuit parameters, we will generally give first priority to establishing a bias to also achieve a particular $g_{m}$. For a bipolar transistor this means that we bias to obtain a specific quiescent collector current because $g_{m}$ is directly proportional to $I_{c}$, as we know from Eq. (8.53b), which is rewritten here:

$$
\begin{equation*}
g_{m}=\frac{q\left|I_{c}\right|}{k T} \tag{11.1}
\end{equation*}
$$

For a field effect transistor in its forward active region (i.e., in saturation), the transconductance $g_{m}$ can be viewed as being proportional to either the gate-to-source voltage $V_{G S}$ or the drain current $I_{D}$, as we can see from Eqs. (10.42a) and ( $10.42 b$ ), which we rewrite here:

$$
\begin{gather*}
g_{m}=K\left|V_{G S}-V_{T}\right|  \tag{11.2}\\
g_{m}=\sqrt{2 K\left|I_{D}\right|} \tag{11.3}
\end{gather*}
$$

The latter expression involves only one device variable, $K$, so it is preferred to the first, which involves both $V_{T}$ and $K$. Thus we typically bias field effect transistors to achieve a specific value of $I_{D}$.

To summarize, the primary objectives of biasing are (1) to place the transistor in its forward active region and (2) to set $g_{m}$ by establishing the quiescent value of the output current (i.e., $I_{C}$ or $I_{D}$ ). We will look at biasing each type of transistor in turn below.

### 11.1.1 Bipolar Transistor Biasing

Our objective in biasing a bipolar transistor for small-signal linear circuit applications is to establish a specific value of quiescent collector current. Perhaps the simplest way to do this, conceptually at least, is to connect a current source to the collector terminal, as illustrated in Fig. 11.1a for an npn bipolar transistor.*

[^10]

FIGURE 11.1
Use of a current source to establish a specific quiescent collector current. The current source is shown connected: (a) to the collector terminal; (b) to the emitter terminal (the only viable option of these three); (c) to the base terminal.

Unfortunately, the circuit in Fig. 11.1a turns out to be impossible to implement because it places too many constraints on the transistor. Specifically, there is no easy way to provide the base current without rendering the circuit useless. Thus, the circuit of Fig. $11.1 a$ is not a viable bias scheme.*

Although we cannot set $I_{c}$ directly with a current source, it is possible to put the current source in the emitter circuit, as illustrated in Fig. 11.1b. The emitter and collector currents are related as

$$
\begin{equation*}
I_{C}=I_{E} \frac{\beta_{F}}{\left(\beta_{F}+1\right)} \tag{11.4}
\end{equation*}
$$

so setting the value of $I_{E}$ sets $I_{C}$. In fact, in a high-gain transistor (i.e., $\beta_{F} \gg 1$ ), the collector and emitter currents are essentially equal; that is,

$$
\begin{equation*}
I_{C} \approx I_{E} \tag{11.5}
\end{equation*}
$$

Yet another biasing option is to apply the current source to the base terminal, as shown in Fig. 11.1c, and to use the relationship

$$
\begin{equation*}
I_{C}=\beta_{F} I_{B} \tag{11.6}
\end{equation*}
$$

Doing this is theoretically possible, but it is not a wise choice as a practical matter. As a general rule of thumb, the current gain $\beta_{F}$ of a bipolar transistor

[^11]is not a very reliable design parameter. $\beta_{F}$ is fixed for a given transistor, to be sure, but it can vary widely from device to device depending on the specific production run or lot the device comes from. Transistors from a particular process may have a mean $\beta_{F}$ of 100 but a standard deviation of 25 to 50 , for example. Thus experience teaches us that it is best to develop circuit designs that rely not on specific values of $\beta_{F}$ but simply on the fact that $\beta_{F}$ is large. Thus using a current source to establish $I_{C}$ through setting $I_{E}$ is good design, whereas trying to establish a value of $I_{C}$ by specifying $I_{B}$ is risky at best.

Another important reality of circuit design is that we tend to have voltage sources available for our primary external bias supplies and that we must build current sources in our circuit where we need them. This typically requires the use of active devices (i.e., transistors), which is not a big problem in an integrated circuit where transistors are small and cheap, but is a costly approach for circuits assembled from discrete devices where resistors are inexpensive and transistors are costly. Thus most nonintegrated circuits, as well as circuits used to make the current sources in integrated circuits, use resistor biasing, which we will discuss next.

A logical place to start when thinking about resistor biasing of a bipolar transistor is with the Ebers-Moll model (see Fig. 8.7). Looking at this model, you could reasonably assume that you want to establish a quiescent value of the base-emitter voltage $V_{B E}$, which would then fix $I_{E}$ and thereby $I_{C}$ (assuming that $\beta_{F}$ is large). A way to do this using a voltage divider is illustrated in Fig. 11.2a. Again, however, practical considerations make this an unwise approach. The parameters involved, namely $I_{E S}$ and $\alpha_{F}$, are difficult to control from transistor to transistor, just as $\beta_{F}$ is. Furthermore, because of the exponential nature of diode characteristics, $I_{E}$ is too sensitive to $V_{B E}$ even in an ideal transistor to make this a viable approach. A much better approach to biasing is to find schemes that are relatively insensitive to the precise value of $V_{B E}$.

Consider next the circuit of Fig. 11.2b, in which one of the bias resistors in the circuit of Fig. $11.2 a$ has been eliminated. We know from our discussion of large-signal bipolar transistor equivalent circuit models that the base-emitter voltage is inevitably about 0.6 V . If the supply voltage is much larger than this, the base current will not vary much even if $V_{B E}$ varies by $\pm 0.05 \mathrm{~V}$ or even $\pm 0.1 \mathrm{~V}$. To examine this further we use the large-signal equivalent circuit model of Fig. $8.19 a$, to proceed with our bias point analyses. Since $V_{B E}$ is essentially 0.6 V , we know that the base current is essentially

$$
\begin{equation*}
I_{B} \approx \frac{\left(V_{C C}-0.6\right)}{R_{B}} \tag{11.7}
\end{equation*}
$$

and thus

$$
\begin{equation*}
I_{C} \approx \beta_{F} \frac{\left(V_{C C}-0.6\right)}{R_{B}} \tag{11.8}
\end{equation*}
$$

These results are not particularly sensitive to the base-emitter voltage, as we anticipated, and in this sense this design is an improvement. However, we


FIGURE 11.2
Three possible circuits for resistively biasing a bipolar transistor: (a) the base-emitter voltage is set by a voltage divider; (b) the base current is set; (c) the emitter current is set (the preferred option).
have already said that $\beta_{F}$ is an unreliable design parameter and that we should not design circuits based on its specific value. Thus this is still not a good bias scheme.

A better approach is to return to the voltage divider of Fig. $11.2 a$ and to add a resistor to the emitter terminal, as illustrated in Fig. 11.2c. Now the important voltage drop is that due to the emitter current and the value of the base current is unimportant, as long as it is small. To see this, notice first that the resistors $R_{B 1}$ and $R_{B 2}$ form a voltage divider that sets the voltage on the base terminal relative to ground. The idea is to make this voltage drop, which is approximately $I_{E} R_{E}+V_{B E}$, much greater than $V_{B E}(\approx 0.6 \mathrm{~V})$, so that any variation in $V_{B E}$ will be reflected as only a small variation in $I_{E}$.

To proceed with our analysis we make several assumptions that are consistent with the governing assumption, namely that we are analyzing a well-designed circuit. First, we assume that the transistor is properly biased in its forward active region and thus that $V_{B E}$ is approximately 0.6 V . Second, we assume that the transistor is a high-gain device and that the base current $I_{B}$ is small compared to $I_{E}$ and $I_{C}$. Finally, we assume that $R_{B 1}$ and $R_{B 2}$ have been chosen so that the current through them is much larger than the base current $I_{B}$. In this case, then, the bias current can be neglected and the voltage between the base and ground (i.e., the voltage drop across $\left.R_{B 2}\right)$ is approximately $R_{B 2} V_{C C} /\left(R_{B 1}+R_{B 2}\right)$. We can thus write

$$
\begin{equation*}
\frac{R_{B 2} V_{C C}}{\left(R_{B 1}+R_{B 2}\right)} \approx I_{E} R_{E}+0.6 \tag{11.9}
\end{equation*}
$$

By using a bit of algebra and setting $I_{C}$ equal to $I_{E}$, we get

$$
\begin{equation*}
I_{C} \approx \frac{R_{B 2} V_{C C} /\left(R_{B 1}+R_{B 2}\right)-0.6}{R_{E}} \tag{11.10}
\end{equation*}
$$

As a practical matter we typically choose $I_{E} R_{E}$ to be 2 or 3 V , and $R_{B 1}$ and $R_{B 2}$ so that $V_{C C} /\left(R_{B 1}+R_{B 2}\right)$ is at least 10 times $I_{B}$. The final point we must check is that the transistor is not saturated; that is, that the base-collector junction is not forward biased, at least not by more than 0.4 V . Since we now know $I_{C}$, we can easily calculate the voltage drop across the resistor $R_{C}$, and thus calculate the base-collector and/or collector-emitter voltage to confirm a proper bias.

## Example

Question. Consider an npn bipolar transistor biased using the circuit illustrated in Fig. 11.2c. Assume for the transistor that $\beta_{F}$ is 75 and $V_{B E, \text { on }}$ is 0.6 V . Assume also that $V_{C C}$ is 9 V and $R_{C}$ is $3 \mathrm{k} \Omega$. Choose $R_{E}, R_{B 1}$, and $R_{B 2}$ so that $I_{C}$ is 1 mA .

Discussion. Since $R_{C}$ is specified, the first step is to calculate the quiescent voltage on the collector, which then tells us the maximum voltage we can have at the emitter. The issue is not simply biasing the transistor in its forward active region, but also ensuring that the transistor will not saturate when it is amplifying an input signal. The quiescent voltage drop across $R_{C}$ is 3 V , so the collector is at 6 V relative to ground; this restricts the positive output swing to 3 V . To achieve the same bound on the negative swing, the bias should be consistent with a collector voltage as low as 3 V . The upper limit on the emitter voltage is thus 2.8 V . If we conservatively choose the emitter bias to be $2.5 \mathrm{~V}, R_{E}$ must be $2.5 \mathrm{k} \Omega$.

The quiescent voltage on the base terminal is 3.1 V (i.e., $2.5+0.6$ ); this gives us one constraint on $R_{B 1}$ and $R_{B 2}$, that is, $R_{B 1} /\left(R_{B 1}+R_{B 2}\right)=3.1 / 9$. The other constraint is set by requiring a quiescent current through $R_{B 1}$ and $R_{B 2}$ at least an order of magnitude larger than the base current of roughly $15 \mu \mathrm{~A}$. Doing this we find that ( $R_{B 1}+R_{B 2}$ ) must be less than $60 \mathrm{k} \Omega$. We find that an $R_{B 1}$ of $21 \mathrm{k} \Omega$ and an $R_{B 2}$ of $39 \mathrm{k} \Omega$ are acceptable.

It is interesting to consider the sensitivity of this bias scheme to $V_{B E, \text { on }}$. If $V_{B E \text {, on }}$ varies from 0.5 to 0.7 V , which for this factor is a very large variation, $I_{C}$ varies from 1.04 mA to 0.96 mA , or only $4 \%$. As predicted, the bias point established by this circuit is relatively insensitive to the value of $V_{B E \text {, on }}$.

In this chapter we will tend to use the resistor-biasing scheme of Fig. 11.2c whenever we need a specific bipolar transistor circuit for purposes of illustration or discussion. This is a very common circuit, one you will see often. In Chap. 12, we will use current source biasing and will use the circuit of Fig. 11.1b. This is a very common circuit for use with integrated differential amplifiers.

### 11.1.2 Field-Effect Transistor Biasing

Current sources can be used to bias field effect transistors as well as bipolar transistors, and the FET equivalents to Figs. $11.1 a$ and $b$ should be obvious to you. Getting the necessary current sources, however, still requires active devices, and thus resistor biasing is also widely used.

Field effect transistors differ from bipolar transistors in several important ways that lead to additional techniques for resistor biasing. On the one hand,
there is no gate current to be concerned with, so the gate potential can be set quite precisely using a voltage divider like we used to bias bipolar transistors. On the other hand, the gate-to-source voltage drop is not a simple 0.6 V but instead varies with bias point. Furthermore, the use of a voltage divider can significantly reduce the input resistance of a MOSFET amplifier stage.

Three possible ways of resistively biasing MOSFETs are illustrated in Figs. $11.3 a, b$, and $c . *$ The circuit in Fig. $11.3 a$ uses a voltage divider to set the voltage on the gate relative to ground in a fashion analogous to that used to bias the bipolar transistor in Fig. 11.2c. The idea is that if this voltage, which we call $V_{\mathrm{REF}}$, is much larger than the threshold voltage $V_{T}$, the quiescent drain current will be relatively insensitive to $V_{T}$. We can see this by noting that $V_{G S}=V_{\mathrm{REF}}-I_{S} R_{S}$; $I_{D}$ equals $I_{S}$; and, in saturation, $I_{D}=K\left(V_{G S}-V_{T}\right)^{2} / 2$. Combining these we arrive at a quadratic equation to solve for $I_{D}$ :

$$
\begin{equation*}
V_{\mathrm{REF}}=I_{D} R_{S}+\sqrt{\frac{2 I_{D}}{K}}+V_{T} \tag{11.11}
\end{equation*}
$$

Clearly the larger $V_{\text {REF }}$ is, the less important small uncertainties in $V_{T}$ are. The drawback of this circuit, as we shall see in Sec. 11.4.1, is that it compromises the


FIGURE 11.3
Three methods of resistively biasing an $n$-channel enhancement mode MOS field effect transistor: (a) a voltage divider is used to set a reference voltage on the gate terminal in a manner analogous to the bias in Fig. 11.2c; (b) two voltage sources are required, but the intrinsic high input resistance of field effect transistors is not compromised; (c) a large resistor is used between the drain and gate to automatically place the transistor in saturation.

[^12]potentially very high input resistance of MOSFET amplifier stages. An alternative that does not use any resistors on the gate terminal but in general requires two bias supplies, one positive $\left(+V_{D D}\right)$ and one negative ( $-V_{S S}$ ) relative to ground, is shown in Fig. 11.3b. In this circuit, $V_{S S}$ plays the role of $V_{\text {REF }}$ in the first circuit.

The final step in the design, independent of which of the bias circuits in Figs. $11.3 a$ and $b$ is used, is to calculate the drain-to-source voltage $V_{D S}$ and to verify that the MOSFET is indeed in its forward active region (i.e., in its saturation region).

The final bias circuit in Fig. 11.3 is one that is unique to enhancement-mode FETs. It makes use of the fact that if $V_{G S}=V_{D S}$, then the device is trivially in saturation, that is, $V_{D S}$ is automatically greater than $\left(V_{G S}-V_{T}\right)$. No current flows into the gate terminal, so $R_{G}$ can be made very large, which is important because its magnitude determines the input resistance of this stage. In this case the equation that relates $I_{D}$ to the other circuit parameters is

$$
\begin{equation*}
V_{D D}=I_{D}\left(R_{D}+R_{S}\right)+\sqrt{\frac{2 I_{D}}{K}}+V_{T} \tag{11.12}
\end{equation*}
$$

This is also quadratic in $I_{D}$, but it is worth remembering that when we are designing a circuit we are not usually solving for $I_{D}$ since that is specified as a design objective (i.e., is a "known"). We are more typically trying to determine suitable resistor, and possibly supply, values given a target value for $I_{D}$.

## Example

Question. Consider an $n$-channel MOSFET biased using the circuit in Fig. 11.3b. Assume that the transistor is biased in the saturation region and that $V_{T}$ is 0.9 V and $K$ is $1 \mathrm{~mA} / \mathrm{V}^{2}$. Assume also that $V_{D D}$ is $5 \mathrm{~V},-V_{S S}$ is -5 V , and $R_{D}$ is $3 \mathrm{k} \Omega$. Choose $R_{S}$ to give a quiescent drain current of 1 mA .

Discussion. Assuming that the MOSFET is saturated, $V_{G S}-V_{T}$ must be 1.4 V , from Eq. (10.15b), and thus $V_{G S}$ is 2.3 V . Since the gate is at ground potential, the source voltage must be -2.3 V , and the voltage drop across $R_{S}$ must be 2.7 V ; thus we select $R_{S}$ to be $2.7 \mathrm{k} \Omega$. The device will be biased in saturation as long as $V_{D S}$ is greater than $V_{G S}-V_{T}$. Since the quiescent drain voltage is 2 V relative to ground, i.e. $5 \mathrm{~V}-(3 \mathrm{k} \Omega)(1 \mathrm{~mA}), V_{D S}$ is 4.3 V ; the device is clearly biased in saturation.

The question of the maximum output voltage swing is an interesting one to consider. Clearly the output voltage can go as high as 5 V , so the positive swing is 3 V . The negative swing is determined by the value of $v_{D S}$ that takes the MOSFET out of saturation. It is tempting to say that this occurs when $v_{D S}$ is 1.4 V or when $v_{D}$ is -0.9 V , yielding a maximum negative swing of 2.9 V , but this is not correct. The value of $v_{G S}$ does not stay fixed; instead, it must increase to create the increase in $i_{D}$ that reduces $v_{D S}$. In effect, $\left(v_{G S}-V_{T}\right)$ is increasing while $v_{D S}$ is decreasing, so $v_{D S}$ cannot decrease as much as it would if $v_{G S}$ were fixed at 1.4 V . (We didn't have this problem with BJTs because $v_{B E}$ changes very little. That is, in a BJT very small changes in $v_{B E}$ can cause enormous changes in $i_{C}$. $K$ would have to be much larger for the same thing to be true in this MOSFET example.)

To find out what the lower bound on $v_{D S}$ is, we must know something about the circuit in which it will be used. If we assume that the source will be incrementally
grounded in the circuit, then the source remains at -2.7 V . Thus, at the boundary of saturation where $v_{D S}=\left(v_{G S}-V_{T}\right)$, we have

$$
v_{D S}=5-\frac{R_{C} K v_{D S}^{2}}{2}-(-2.3)
$$

Upon solving this, we find that $v_{D S}$ is 1.95 V and thus that the drain voltage relative to ground, $v_{D S}-2.3$, is -0.35 V , corresponding to a negative voltage swing of 2.35 V . This is significantly less than our first (incorrect) estimate of 2.9 V .

Notice that the small-signal transconductance $g_{m}$ of a field effect transistor always depends on device, as well as bias point, parameters (i.e., $K$ and/or $V_{T}$, as well as $I_{D}$ and/or $V_{G S}$ ). This is in contrast to the situation with bipolar transistors, where we could eliminate the dependence of $g_{m}$ on $\beta$ by making $I_{C}$ largely independent of $\beta_{F}$. This makes it more difficult in practice to design linear amplifiers with field effect transistors for applications that require specific values of gain, which has limited their application in simple amplifier circuits. However, as MOSFET technology has advanced and $K$ and $V_{T}$ have become better controlled, more complicated circuits have become possible; now the use of MOSFETs in high-performance linear integrated circuits has become common. These circuits use current. source biasing to reduce the dependence of $g_{m}$ on $V_{T}$, but the sensitivity to $K$ remains [see Eq. (11.3)].

### 11.2 THE CONCEPT OF MID-BAND

After completing the large-signal analysis and/or design of a linear amplifier circuit to determine the bias point, we will have to turn to an analysis of its small-signal linear operation about that bias point using our small-signal (i.e., incremental) equivalent circuit models. A question we must address first is what model to use.

Usually we will be interested in knowing the small-signal response because we have a time-varying signal that we wish to amplify. Thus we should assume that we must use a model which includes the capacitors we added to extend our initially quasistatic modeling to incorporate energy storage and so that we could treat time-varying signals. That is, we should use the models pictured in Figs. 8.24 and 10.13 . This is a major complication.

The picture is further complicated when we realize that we will find that it is extremely useful to add additional capacitors to our circuits to introduce current paths for time-varying signals that do not exist for the bias currents. We very quickly find ourselves dealing with circuits containing many capacitors, in addition to all of the other resistors and dependent and independent sources; the analysis becomes overwhelming.

Fortunately, we will find that we can make major simplifications. To see how, let us look at a specific example to make sure that first the problem and then the solution are clear.

Consider the circuit shown in Fig. 11.4a. This is a bipolar amplifier that we will see a lot of in this text, but for now we just want to use it to illustrate some general points. The capacitors $C_{I}, C_{O}$, and $C_{E}$ do not conduct non-time-varying


FIGURE 11.4
Resistively biased, capacitively coupled common-emitter bipolar transistor amplifier: (a) the complete circuit schematic; (b) the complete small-signal linear equivalent circuit; (c) the model for mid-band analysis.
(i.e., DC ) currents, so for purposes of biasing the circuit is identical to the circuit in Fig. 11.2c. For small-signal linear operation about a bias point in the forward active region, the equivalent circuit becomes that illustrated in Fig. 11.4b. Here we have used the fact that the incremental signal on the power supply is zero (i.e., the $V_{C C}$ terminal is incrementally grounded), and we have replaced the transistor with its hybrid- $\pi$ equivalent circuit, Fig. $8.28 a$. Looking at Fig. 11.4b, we can count five capacitors. It is clear that unless we can do something dramatic we have a lot of work to do to analyze this circuit.

The key to simplifying the analysis of amplifier circuits like that of Fig. $11.4 b$ is to note that the capacitors in the circuit vary widely in size and to recognize that the impedance of a capacitor varies inversely with frequency. The intrinsic device capacitors, $C_{\pi}$ and $C_{\mu}$, for example, are typically small and have relatively large impedances at the signal frequencies of interest. By "relatively large" we mean that the magnitude of the impedance presented by a given capacitor is so much larger than the equivalent resistance in parallel with it that it can be treated as an open circuit. At sufficiently high frequencies this can no longer be true, of course, but below some limiting frequency, which we call $\omega_{\mathrm{HI}}, C_{\pi}$ and $C_{\mu}$ can be treated as open circuits and effectively neglected.
$C_{I}, C_{O}$, and $C_{E}$ are elements whose values we choose, so they can be made as large or as small as we want. We said earlier that the reason for having these elements in the circuit is to provide additional current paths for the timevarying signals. This means that we want those capacitors to be large, so that their impedance is relatively low at the signal frequencies of interest. By "relatively low" we mean that the magnitude of the impedance of a capacitor is sufficiently lower than the equivalent resistance in series or parallel with it that the capacitor can be treated as a short circuit. There will in general be a frequency limit, which we will call $\omega_{\text {LO }}$, above which the extrinsic capacitors like $C_{I}, C_{O}$, and $C_{E}$ can be treated as short circuits.

The frequency range between $\omega_{\mathrm{LO}}$ and $\omega_{\mathrm{HI}}$ is called the mid-band frequency range. One of the objectives of linear amplifier design is to ensure that there is a mid-band range (i.e., that $\omega_{\mathrm{HI}}$ is greater than $\omega_{\mathrm{LO}}$ ) and that the mid-band range encompasses the signal frequencies of interest. We will consider the problem of calculating $\omega_{\mathrm{LO}}$ and $\omega_{\mathrm{HI}}$ in Chap. 14. For now, we will assume that there is a mid-band range and that we are operating in it. In this case the circuit in Fig. $11.4 b$ reduces to that shown in Fig. 11.4c. No capacitors remain. $C_{\pi}$ and $C_{\mu}$ have been replaced by open circuits; and $C_{I}, C_{O}$, and $C_{E}$ have been replaced by short circuits.

In summary, we will concentrate on analyzing the mid-band performance of linear amplifiers. In the mid-band range all of the capacitors are effectively either short or open circuits and do not appear in the analysis. The transistor models that we must use for mid-band analysis are the low-frequency incremental equivalent circuit models (i.e., those in Figs. 8.24 and 10.15).

### 11.3 SINGLE-BIPOLAR-TRANSISTOR AMPLIFIERS

As we look at various single-transistor amplifier stages, we will want to consider certain important performance characteristics as a way of evaluating their usefulness for various applications. The first such useful small-signal linear amplifier characteristic is the mid-band voltage gain $A_{\nu}$, which is defined as the ratio of the incremental output and input voltages (see Fig. 11.4c):

$$
\begin{equation*}
A_{v} \equiv \frac{v_{\text {out }}}{v_{\text {in }}} \tag{11.13}
\end{equation*}
$$

In certain situations, it is useful to also introduce the concept of open-circuit voltage gain $A_{v, o c}$, which is defined as the value of $A_{v}$ when $R_{L}$ (see Fig. 11.4c) is infinite (i.e., with the output terminals open-circuited). The corresponding output voltage $v_{\text {out,oc }}$ is the Thevenin equivalent voltage seen when looking back in at the output terminals; clearly, $v_{\text {out }, o c}=A_{v, o c} v_{\text {in }}$.

We also define mid-band current gain $A_{i}$ as

$$
\begin{equation*}
A_{i} \equiv \frac{i_{\mathrm{out}}}{i_{\mathrm{in}}} \tag{11.14}
\end{equation*}
$$

Again, we can speak of a short-circuit current gain $A_{i, \mathrm{sc}}$, which is the value of $A_{i}$ when $R_{L}$ is a short circuit. You will recognize the corresponding output current as the Norton equivalent current seen when looking back in at the output terminals; clearly, $A_{\text {out,sc }}=A_{i, s c} i_{\text {in }}$.

The mid-band power gain $A_{p}$ is defined as

$$
\begin{equation*}
A_{P} \equiv \frac{p_{\text {out }}}{p_{\text {in }}}=\frac{v_{\text {out }} i_{\text {out }}}{v_{\text {in }} i_{\mathrm{in}}}=A_{\nu} A_{i} \tag{11.15}
\end{equation*}
$$

where $p_{\text {out }}$ is $v_{\text {out }} i_{\text {out }}$ and $p_{\text {in }}$ is $\nu_{\text {in }} i_{\text {in }}$. Equation (11.15) shows that the power gain $A_{p}$ can also be written as the product of $A_{v}$ and $A_{i}$.

Additional characteristics of interest are the input and output resistances. The mid-band input resistance $R_{\mathrm{in}}$ is defined as

$$
\begin{equation*}
R_{\mathrm{in}} \equiv \frac{v_{\mathrm{in}}}{i_{\mathrm{in}}} \tag{11.16}
\end{equation*}
$$

$R_{\text {in }}$ is an important parameter because it provides us with a measure of how much the amplifier will load the input source. Referring to Fig. $11.4 c$, we see that $v_{\text {in }}$ is related to $v_{t}$ as

$$
\begin{equation*}
v_{\mathrm{in}}=\frac{R_{\mathrm{in}}}{R_{T}+R_{\mathrm{in}}} v_{t} \tag{11.17}
\end{equation*}
$$

Clearly, if we want the largest possible output signal $v_{\text {out }}$ for a given source signal $v_{t}$, we also want the largest possible $\nu_{\text {in }}$ for a given $v_{t}$. That is, we want $R_{\text {in }}$ to be much larger than $R_{T}$, so $v_{\text {in }}$ is essentially $v_{t}$. Input loading is an important factor to keep in mind as you study linear amplifiers. We will choose to think of the voltage gain as $v_{\text {out }} / v_{\text {in }}$ rather than as $v_{\text {out }} / v_{t}$, so we must remember that our expressions may not reflect the negative impact of $R_{\text {in }}$ and $R_{T}$ seen in Eq. (11.17).

The mid-band output resistance $R_{\text {out }}$ is defined as the resistance seen when looking back in at the output terminals with zero input signal. $R_{\text {out }}$ is clearly also the Thevenin equivalent resistance of the amplifier seen when looking back in at the output terminals at mid-band.

We will now turn to the study of four single-transistor bipolar amplifier stages: the common-emitter, degenerate-emitter, common-base, and emitterfollower stages. After discussing these four stages here and similar field effect transistor stages in Sec. 11.4, we will conclude by comparing and contrasting all of these stages in Sec. 11.5.

### 11.3.1 Common-Emitter Stage

In the common-emitter stage an input voltage signal is applied to the base terminal of the transistor, the output voltage is taken from the collector terminal, and the emitter terminal is grounded (at mid-band frequencies). The output voltage is created by the collector current flowing through a device or circuit we call the load. This load can take several forms. We will first look at common-emitter stages in which a passive linear resistive network is connected to the collector as the load. Then we will look at circuits in which more complicated "active" devices, such as other transistors, are used as the load.
a) Linear resistor loads. We have already seen a resistively biased, capacitively coupled version of a common-emitter stage with a linear resistor load in Fig. 11.4a. To analyze the small-signal mid-band performance of this amplifier we use the circuit pictured in Fig. 11.4c. For convenience we redraw this commonemitter amplifier and its mid-band small signal linear equivalent circuit in Fig. 11.5. Notice that we have included the parasitic base series resistance $r_{x}$ and the output resistance $r_{o}$ in Fig. $11.5 b$ because we do not know yet whether they can be neglected.


FIGURE 11.5
(a) Common-emitter bipolar transistor amplifier; (b) the small-signal linear equivalent circuit at mid-band, including $r_{x}$ and $r_{o}$.

Looking first at the voltage gain, we see from Fig. $11.5 b$ that $v_{\text {out }}$ is given by

$$
\begin{equation*}
\nu_{\text {out }}=-g_{m} v_{\pi} R_{L}^{\prime} \tag{11.18}
\end{equation*}
$$

where $R_{L}^{\prime}$ is the equivalent of resistors $r_{o}, R_{C}$, and $R_{L}$ in parallel; that is,

$$
\begin{equation*}
R_{L}^{\prime} \equiv r_{o}\left\|R_{C}\right\| R_{L} \tag{11.19}
\end{equation*}
$$

Next, we see that $v_{\pi}$ can be related to $v_{\text {in }}$ as

$$
\begin{equation*}
v_{\pi}=\frac{r_{\pi}}{r_{\pi}+r_{x}} v_{\mathrm{in}} \tag{11.20a}
\end{equation*}
$$

In a modern transistor $r_{x}$ is typically 25 to $30 \Omega$; if $\beta_{f}$ is 50 or more and $I_{C}$ is on the order of $1 \mathrm{~mA}, r_{\pi}$ will be greater than $1 \mathrm{k} \Omega$, so that to a good approximation we can write

$$
\begin{equation*}
v_{\pi} \approx v_{\mathrm{in}} \tag{11.20b}
\end{equation*}
$$

Substituting these results in Eq. (11.18) we arrive at the following expression for the voltage gain:

$$
\begin{equation*}
A_{v}=-g_{m} R_{L}^{\prime} \tag{11.21}
\end{equation*}
$$

A frequent objective of a circuit designer is to make $A_{v}$ as large as possible, so let us now see how big we can make $A_{v}$. Looking at Eq. (11.21), we see that we want to make both $g_{m}$ and $R_{L}^{\prime}$ as large as possible. Looking first at $R_{L}^{\prime}$, we see that it will essentially equal the smallest of $r_{o}, R_{C}$, and $R_{L}$. Assuming we have already chosen the transistor with the highest available $r_{o}$, the only quantities we can change are $R_{C}$ and $R_{L}$. If we make $R_{C}$ and $R_{L}$ much larger than $r_{o}, R_{L}^{\prime}$ will be approximately $r_{0}$ and $A_{v}$ will be maximized for this particular transistor at

$$
\begin{equation*}
A_{v, \max } \approx-g_{m} r_{o} \tag{11.22}
\end{equation*}
$$

Both $g_{m}$ and $r_{0}$ are functions of the bias point, so we next consider what bias point makes $A_{\nu, \max }$ largest. Recalling that $g_{m}$ is $q I_{C} / k T$ and $r_{o}$ is $\left|V_{A}\right| / I_{C}$, where $V_{A}$ is the Early voltage of the transistor, we find that in terms of the bias point, Eq. (11.22) can also be written as

$$
\begin{equation*}
A_{v, \max } \approx-\frac{q\left|V_{A}\right|}{k T} \tag{11.23}
\end{equation*}
$$

Interestingly, the collector bias current $I_{C}$ does not appear in this expression. Thus, the maximum voltage gain we can ever get from a given transistor in a common-emitter connection is determined solely by its Early voltage (and the operating temperature). This gain can be very large. For example, a transistor with an Early voltage of 50 V has an $A_{v, \max }$ of 2000 at room temperature.

The collector bias current $I_{C}$ does not appear explicitly in Eq. (11.23), but it is lurking in the background because we have already assumed that $R_{C}$ and $R_{L}$ are much greater than $r_{0}$ and because $r_{0}$ depends on $I_{C}$. Thus if $I_{C}$ is too small, $r_{o}$ will be too large, and our assumption that it is less than $R_{C}$ and $R_{L}$ will no longer be valid. The implication is that we must make $I_{C}$ greater than some minimum value, but there is also a problem in making it large. Specifically,
if $I_{C}$ is large, the quiescent voltage drop across $R_{C}$ will be too large, and the transistor will be saturated. To see this, look back at Fig. $11.4 a$ (you may also want to review the example on page 322). To keep the transistor biased in its forward active region, the voltage drop across $R_{C}$ must be less than some value, call it $V_{C, \text { max }}$, and thus we must have

$$
\begin{equation*}
I_{C} R_{C}<V_{C, \operatorname{MAX}} \tag{11.24a}
\end{equation*}
$$

or

$$
\begin{equation*}
I_{C}<\frac{V_{C, \operatorname{MAX}}}{R_{C}} \tag{11.24b}
\end{equation*}
$$

This in turn places a restriction on $r_{o}$; that is, we have

$$
\begin{equation*}
r_{o}=\frac{\left|V_{A}\right|}{I_{C}}>\frac{\left|V_{A}\right|}{V_{C, \mathrm{MAX}}} R_{C} \tag{11.25}
\end{equation*}
$$

which says that to have $R_{C}$ greater than $r_{o}$, we must have $V_{C, \text { MAX }}$ greater than $\left|V_{A}\right|$.

Now we have a problem. $V_{C, \text { MAX }}$ is determined by the power supply voltage $V_{C C}$ and the desired output voltage swing, and it is typically at most a few tens of volts. At the same time, $\left|V_{A}\right|$ in a good transistor is several tens or even hundreds of volts. Typically then $\left|V_{A}\right|$ is at worst comparable to $V_{C, M A X}$, and frequently is much larger than $V_{C, \mathrm{MAX}}$, so making $R_{C}$ much greater than $r_{o}$ is impossible!* We will see how to get around this problem by using nonlinear active loads in the next subsection, but for now where we are using linear resistors, we cannot have $r_{o}$ much less than $R_{C}$ and $R_{L}$, and we cannot get a gain as large as $A_{v, \max }$ in Eqs. (11.22) and (11.23).

If $R_{C}$ and $R_{L}$ are in fact restricted to be much less than $r_{o}$, as we have just seen they will be if we have a good transistor with a reasonable Early voltage, $R_{L}^{\prime}$ in Eq. (11.19) will be more nearly $R_{C}$ in parallel with $R_{L}$ than $r_{o}$, and our voltage gain expression is now approximately

$$
\begin{equation*}
A_{v} \approx \frac{g_{m} R_{C} R_{L}}{R_{C}+R_{L}} \tag{11.26}
\end{equation*}
$$

or, using the bias dependence of $g_{m}$,

$$
\begin{equation*}
A_{v} \approx-\frac{q I_{C} R_{L}^{\prime}}{k T}=-\frac{q}{k T} \frac{I_{C} R_{L} R_{C}}{R_{L}+R_{C}} \tag{11.27}
\end{equation*}
$$

Again using our restriction on the $I_{C} R_{C}$ product [i.e., Eq. (11.24a)], we have

$$
\begin{equation*}
A_{\nu}<-\frac{q}{k T} \frac{V_{C, \mathrm{MAX}} R_{L}}{\left(R_{C}+R_{L}\right)} \tag{11.28}
\end{equation*}
$$

[^13]Clearly, to make $A_{\nu}$ large we want to keep the product $I_{C} R_{C}$ as large as possible, but within this constraint we still have the freedom to make $I_{C}$ small and $R_{C}$ large, or vice versa. Looking at Eq. (11.27), we see that the best choice, if we want to increase $A_{y}$, is to reduce $R_{C} . I_{\mathcal{C}}$ will have to be increased correspondingly to keep the $I_{C} R_{C}$ product at its maximum value, of course, and this increases the power dissipation in the stage and reduces its input resistance (see below), both of which may be undesirable consequences. Notice also that once $R_{C}$ is reduced to less than roughly a tenth of $R_{L}$, little is gained by reducing it further since the factor $R_{L} /\left(R_{C}+R_{L}\right)$ will already be just about as large as it can ever get (i.e., approximately 1 ).

Increasing the size of the bias supply $V_{C C}$ is a way to increase the bound on the $I_{C} R_{C}$ product and thus is another way to increase $A_{\nu}$, but doing so also increases the power dissipation in the circuit and is not always an attractive or practical solution. A far better solution is to use an active load, as we shall see in the next subsection; the "cost" of doing this comes in terms of circuit complexity and device count rather than power or other performance parameters.

Returning to our characterization of the common-emitter amplifier stage, the easiest way to determine the mid-band current gain is to first think of the dependent current source as $\beta_{F} i_{b}$ rather than $g_{m} v_{\pi}$, and to notice that $-i_{\text {out }}$ is the fraction of this current flowing through $R_{L}$, or $\beta_{F} i_{b} R_{C} /\left(R_{L}+R_{C}\right)$, assuming $r_{0}$ is so large that it can be neglected. Next notice that $i_{b}$ is the fraction of $i_{\text {in }}$ flowing through $r_{\pi}$, which is $i_{\text {in }} R_{B}^{\prime} /\left(R_{B}^{\prime}+r_{\pi}\right)$, assuming $r_{x}$ can be neglected. (Here $R_{B}^{\prime}$ is the parallel combination of $R_{B 1}$ and $R_{B 2}$.) By substituting this latter expression for $i_{b}$ in the former expression for $i_{\text {out }}$ and dividing by $i_{\text {in }}$, we arrive at.

$$
\begin{equation*}
A_{i}=-\beta_{F} \frac{R_{C}}{\left(R_{L}+R_{C}\right)} \frac{R_{B}^{\prime}}{\left(R_{B}^{\prime}+r_{\pi}\right)} \tag{11.29}
\end{equation*}
$$

Notice that $A_{i}$ is always less than $\beta_{F}$, but in the limit of $R_{L}$ much smaller than $R_{C}$ and of $R_{B}^{\prime}$ much larger than $r_{\pi}, A_{i}$ becomes very nearly $\beta_{F}$. Of course, making $R_{L}$ very small means that the voltage gain is also very small, so clearly choices must be made in the design of the stage depending on the performance objectives.

The power gain $A_{p}$ is the product of $A_{v}$ and $A_{i}$. It is maximized when $R_{B}^{\prime}$ is much larger than $r_{\pi}$ and when $R_{C}=R_{L}$, in which case

$$
\begin{equation*}
A_{p, \max }=\frac{\beta_{F} g_{m} R_{C}}{4} \tag{11.30a}
\end{equation*}
$$

or, equivalently,

$$
\begin{equation*}
A_{p, \max }=\frac{q \beta_{F} I_{C} R_{C}}{4 k T} \tag{11.30b}
\end{equation*}
$$

Notice again the importance of the quiescent voltage drop across the collector resistor, $I_{C} R_{C}$.

The input resistance of this stage is $R_{B}^{\prime}$ in parallel with $r_{\pi}$, and the output resistance is $R_{C}$. In a typical common-emitter amplifier $R_{B}^{\prime}$ will be much larger
than $r_{\pi}$, so $R_{\text {in }}$ is essentially $r_{\pi}$ and depends on the bias point as $\beta_{F} k T / q I_{C}$. As we have said earlier, this is typically on the order of a thousand ohms. Notice also that making $I_{C}$ larger reduces $R_{\mathrm{in}}$, as we mentioned above.

## Example

Question. Assume that we have a common-emitter amplifier like that in Fig. 11.5a, biased with $I_{C}=1 \mathrm{~mA}$, using the supply and resistor values from our earlier example; that is, $V_{C C}=9 \mathrm{~V}, R_{C}=3 \mathrm{k} \Omega, R_{E}=2.5 \mathrm{k} \Omega, R_{B 1}=21 \mathrm{k} \Omega$, and $R_{B 2}=39 \mathrm{k} \Omega$. Assume also that $R_{L}$ is $3 \mathrm{k} \Omega$. What are the mid-band incremental voltage gain, current gain, power gain, and input resistance?

Discussion. The transconductance $g_{m}$ for this bias point is 40 mS , and $r_{\pi}$ is $1.88 \mathrm{k} \Omega$. Applying our formulas we calculate that $R_{L}^{\prime}$ is $1.5 \mathrm{k} \Omega$, so $A_{y}$ is -60 , $A_{i}$ is -18.75 , and $A_{p}$ is 1125 . The input resistance is $1.65 \mathrm{k} \Omega$. These results will have more meaning to us after we discuss other amplifier stages in the next several sections.

To summarize the properties of the common-emitter stage with a linear resistor load, this stage can have significant amounts of both voltage and current gain. Its input resistance is typically $r_{\pi}$, which is often relatively low, and its output resistance is $R_{C}$.
b) Nonlinear and active loads. The voltage and power gains of the commonemitter amplifier are limited by the quiescent voltage drop across the collector resistor $R_{C}$ caused by the quiescent collector current $I_{C}$ flowing through it: the infamous $I_{C} R_{C}$ product, or $V_{C, \text { MAX }}$. For a given $R_{C}$, increasing $I_{C}$ (to increase $g_{m}$, for example) reduces the magnitude of the permissible output voltage swing; and, as we have already pointed out, if the $I_{\mathcal{C}} R_{C}$ product is made too large, the transistor will be saturated. Thus the $I_{C} R_{C}$ product can be only so large. As a practical matter, we find in many designs that $I_{C} R_{C}$ turns out to be on the order of $V_{C C} / 2$ or $V_{C C} / 3$.

A way around this dilemma is illustrated in Fig. 11.6. The idea (as shown in Fig. 11.6a) is to use a collector bias element in place of $R_{C}$ that is nonlinear and for which the incremental resistance at the bias point, $d v_{A B} /\left.d i_{D}\right|_{Q}$, is much larger than the ratio of the quiescent terminal voltage and current, $V_{A B} / I_{D}$, as shown in Fig. 11.6b. If we define the incremental resistance of this nonlinear element at its bias point as $r_{c}$, that is,

$$
\begin{equation*}
\left.r_{c} \equiv \frac{d v_{A B}}{d i_{D}}\right|_{Q} \tag{11.31}
\end{equation*}
$$

then the incremental equivalent circuit of the amplifier is that illustrated in Fig. $11.6 c$. Now there is no bias-related restriction on the magnitude of $r_{c}$. If $r_{c}$ and $R_{L}$ are much greater than $r_{o}$, the voltage gain of the stage can indeed be the $A_{v, \text { max }}$ we defined earlier in Eq. (11.22), that is,

$$
\begin{equation*}
A_{v}=A_{v, \max }=-g_{m} r_{o} \tag{11.32}
\end{equation*}
$$



FIGURE 11.6
(a) Common-emitter circuit with a nonlinear element (NE) as a load; (b) the current-voltage characteristics sought for such a load; (c) the small-signal linear equivalent model for this circuit.

Since achieving this gain relies on $R_{L}$ being very large, it is convenient at this point to recall that the definition of open-circuit voltage gain $A_{v, o c}$ is the gain of the stage with the output terminals open-circuited (i.e., with $R_{L}$ infinite). Thus, what we want to be talking about is the open circuit voltage gain, and for the common-emitter stage in Fig. 11.6 we have

$$
\begin{equation*}
A_{\nu, o c}=-g_{m} \frac{r_{o} r_{c}}{r_{o}+r_{c}} \tag{11.33}
\end{equation*}
$$

In the limit of $r_{c} \gg r_{o}$, this approaches $A_{\nu, \max }$.
As far as finding a suitable nonlinear load is concerned, there are many nonlinear devices, some active and some passive, that have the property illustrated in Fig. $11.6 b$ (and there are many, such as $p-n$ diodes, that do not), but most nonlinear devices tend to be active. In fact, a near-ideal device for this application is a current source, and we can make excellent current sources using transistors. An example is shown in Fig. 11.7, where a bipolar transistor current source circuit is used to bias a bipolar common-emitter stage. (We will see additional examples involving FET amplifier stages later in Sec. 11.4.)


FIGURE 11.7
Use of $n p n$ and $p n p$ bipolar transistors as loads: (a) the idea of a BJT as a current source, showing in (i) that fixing the base-emitter voltage of a high- $\beta$ transistor at $V_{\mathrm{REF}}$ fixes its collector current at $I_{L}=I_{E S} e^{q \gamma_{\text {REF }} / k T}$ and showing in (ii) that the corresponding incremental equivalent circuit reduces simply to $r_{0} ;(b)$ a common-emitter amplifier stage with a bipolar transistor current source replacing $R_{C}$ in the collector circuit; (c) the corresponding mid-band small-signal linear equivalent circuit. Notice that a numerical subscript has been added to the equivalent circuit parameters to indicate to which transistor in the circuit they correspond.

The circuit in Fig. 11.7a illustrates the basic concept: a bipolar transistor with a fixed base-emitter voltage $V_{B E}$ looks like a current source when viewed at the collector terminal, as long as the transistor is in its forward active region. This is illustrated in Fig. $11.7 a(\mathrm{i})$ where $V_{B E}$ is fixed at $V_{\mathrm{REF}}$, and the value of the current source $I_{L}$ is approximately $I_{E S} e^{q V_{\mathrm{REF}} / k T}$. With respect to mid-band frequency signals, then, this device looks like a transistor with no incremental base-emitter voltage (i.e., $v_{b e}$ is zero), and the only element seen between the collector and emitter is the output resistance $r_{o}$. This is illustrated in Fig. 11.7a(ii). Consequently, the incremental resistance of this load $r_{c}$, is $r_{o}$.

Implementing this type of current souce load is somewhat complicated in practice, albeit straightforward, as the circuit in Figure $11.7 b$ helps illustrate. The complexity arises because the collector current of the transistor we are loading, $Q_{1}$, is already set by its bias network (i.e., $R_{B 11}, R_{B 21}$, and $R_{E 1}$ ) and if the value of the load current souce $I_{L}$ is not identical to $I_{C 1}$, either $Q_{1}$ or $Q_{3}$ will saturate. It would be easy to set $I_{L}$ equal to $I_{C 1}$ if we knew $I_{E S}$ for $Q_{3}$, but a circuit designer can never rely on knowing $I_{E S}$ with any accuracy. The best we can do is to rely on the fact that in an integrated circuit we can comfortably assume that devices having the same size and shape will have essentially identical characteristics. Thus if we duplicate the network biasing $Q_{1}$ and use it to bias an identical transistor $Q_{2}$, then the collector current of $Q_{2}$ will equal that of $Q_{1}$. Then we can use $I_{C 2}$, the collector current of $Q_{2}$, to establish $V_{\text {REF }}$ by using $I_{C 2}$ to bias $Q_{4}$, a transistor that is identical to the current source load transistor $Q_{3}$. Doing this, $V_{B E 4}$ becomes the $V_{\text {REF }}$ we seek, and with this value of $V_{\text {REF }}$ we have $\left|I_{C 3}\right|=\left|I_{C 4}\right| \approx I_{C 2}=I_{C 1}$.

Notice that we did not say $\left|I_{C 3}\right|$ and $\left|I_{C 4}\right|$ equal $I_{C 2}$ and $I_{C 1}$, but only that they are similar. The descrepency arises because we have to account for the base currents of $Q_{3}$ and $Q_{4}$. In the circuit in Fig. 11.7b, the base currents for $Q_{3}$ and $Q_{4}$ are supplied by the transistor $Q_{5}$, which has been connected between the base and collector of $Q_{4}$, and the base current of $Q_{5}$ is supplied by $Q_{2}$. Summing the currents into the collector of $Q_{2}$, we find that because of this base current, $\left|I_{C 4}\right|$ is not exactly $I_{C 2}$, so $\left|I_{C 3}\right|$ is not exactly $I_{C 1}$. Instead $\left|I_{C 4}\right|$ is related to $I_{C 2}$ through $I_{C 2}=\left|I_{C 4}\right|+\left|I_{B 5}\right|$. Pursuing this further, since $I_{B 5}$ is $\left(I_{B 3}+I_{B 4}\right) / \beta_{5}$ and since $I_{B 3}$ and $I_{B 4}$ are both $I_{C 3} / \beta_{3}$ (recall that $Q_{3}$ and $Q_{4}$ are identical and that $I_{C 3}=I_{C 4}$ ), we can write $I_{C 1}=I_{C 2}=\left|I_{C 3}\right|\left(1+2 / \beta_{3} \beta_{5}\right) \approx\left|I_{C 3}\right|$ (if $\beta_{3}$ and $\beta_{5}$ are large). Thus, $\left|I_{C 3}\right|$ is not exactly equal to $I_{C 1}$, but it is very, very close if the $\beta$ s are large.

An alternative to using $Q_{5}$ in this circuit is to simply short the base and collector of $Q_{4}$ together (you will find an illustration of this alternative applied to $n p n s$ in Fig. 12.16). When $Q_{5}$ is eliminated and the base and collector of $Q_{4}$ are shorted, $Q_{2}$ must supply the base currents of $Q_{3}$ and $Q_{4}$ directly, and we find that $I_{C 1}=I_{C 2}=\left|I_{C 3}\right|\left(1+2 / \beta_{3}\right)$. In this case, the difference between $I_{C 1}$ and $\left|I_{C 3}\right|$ may be much more significant, and adding $Q_{5}$ is a wise design move,

Summarizing our discussion thus far, the practical implementation of a current source load is more complicated than one might have guessed looking at

Fig. 11.7a, but it can be done straightforwardly in an integrated circuit context where we can safely assume that the characteristics of devices will be matched. Turning now to the incremental analysis of this circuit, the transistor $Q_{3}$ is the current source, and the base-emitter voltage on $Q_{3}$ has a constant value established by $Q_{4}$. Thus the $g_{m 3} v_{\pi 3}$ dependent generator in the hybrid- $\pi$ model for $Q_{3}$ is zero, and the only element between the collector and emitter of the incremental model of $Q_{3}$ is the output resistance $r_{o 3}$, as the sequence in Fig. 11.7a illustrates. The incremental equivalent circuit for the amplifier in Fig. $11.7 b$ is therefore as shown in Fig. 11.7c. Thus, the load resistance $r_{c}$ is now $r_{o 3}$, and the open circuit voltage gain is

$$
\begin{equation*}
A_{\nu, o c}=-g_{m 1} \frac{r_{o 1} r_{o 3}}{r_{o 1}+r_{o 3}} \tag{11.34a}
\end{equation*}
$$

which can also be written as

$$
\begin{equation*}
A_{\nu, o c}=-\frac{g_{m 1}}{g_{o 1}+g_{o 3}} \tag{11.34b}
\end{equation*}
$$

By using the bias point dependences of $g_{m}$ and $g_{o}$ and noting that the magnitude of the quiescent collector current, $\left|I_{C}\right|$, is the same in $Q_{1}$ and $Q_{3}$, we find that Eq. (11.34a) can also be written as

$$
\begin{equation*}
A_{v, \mathrm{oc}}=-\frac{q}{k T} \frac{\left|V_{A 1}\right|\left|V_{A 3}\right|}{\left|V_{A 1}\right|+\left|V_{A 3}\right|} \tag{11.34c}
\end{equation*}
$$

Once again the importance of a large Early voltage, and thereby a large output resistance, is apparent.

A current source load like this is most commonly used with an emitter coupled pair, or differential amplifier, which we shall study in Chap. 12. The circuit in Fig. $11.7 b$ is used in the 741 operational amplifier, for example (a schematic of the 741 circuit is given in Fig. 14.5). In this context, it is also called a current mirror, a subject we will discuss again in Sec. 13.3.

The incremental analysis of the amplifier in Fig. $11.7 b$ is actually the easy part; the more troublesome aspect of the circuit is biasing it. As we discussed earlier, this circuit requires very close matching of the components to be successful: $Q_{2}$ must be identical to $Q_{1}, Q_{4}$ to $Q_{3}, R_{B 12}$ to $R_{B 22}$, etc. Such close matching of components is possible only in integrated circuits where all of the devices are fabricated simultaneously. Even then, however, we must also stabilize the resulting high-gain amplifier in a feedback loop to keep the amplifier from saturating. This is so because the output of any very high-gain amplifier, such as the one we have just presented, will saturate unless the input is very small. At the same time, any imbalance in the circuit (including any imbalance in the components) will function effectively as a virtual input signal that can easily be large enough to saturate the output (i.e., saturate one or more of the transistors in the circuit). As a practical matter then, the only realistic way of using such a "beast" is to put
it in a feedback loop.* This is exactly what you already do with an operational amplifier, for example, when you put a resistor between the output terminal and the negative input terminal. The price you pay is reduced overall gain, but what you buy is an amplifier that works and a gain you can rely on since it is set by passive, linear resistances.

### 11.3.2 Degenerate-Emitter Stage

The common-emitter amplifier stage is an extremely important one that is widely used, but it does have some shortcomings. In particular, its voltage gain is temperature-dependent, its current gain depends directly on $\beta_{F}$, and its input resistance is relatively low. A common solution for these problems is to leave some or all of the emitter bias resistor $R_{E}$ in the small-signal circuit by not shorting it completely with $C_{E}$. The circuit, which is now said to have emitter degeneracy, is illustrated in Fig. 11.8a. The corresponding small-signal incremental equivalent circuit for mid-band analysis is presented in Fig. $11.8 b$.

The analysis of the circuit in Fig. $11.8 b$ is facilitated if we recognize that the current through the resistor $R_{E 1}$ is $\left(g_{m}+g_{\pi}\right) v_{\pi}$. The input voltage $v_{\text {in }}$ is thus equal to $v_{\pi}+R_{E 1}\left(g_{m}+g_{\pi}\right) \nu_{\pi}$, and we can write $v_{\pi}$ as

$$
\begin{equation*}
v_{\pi}=\frac{v_{\mathrm{in}}}{1+R_{E 1}\left(g_{m}+g_{\pi}\right)} \tag{11.35}
\end{equation*}
$$

The output voltage $v_{\text {out }}$ is $-R_{L}^{\prime} g_{m} v_{\pi}$, as it was in the common-emitter stage, so we can immediately write the voltage gain $A_{v}$ as

$$
\begin{equation*}
A_{v}=-\frac{g_{m} R_{L}^{\prime}}{1+R_{E 1}\left(g_{m}+g_{\pi}\right)} \tag{11.36a}
\end{equation*}
$$

By multiplying the numerator and denominator of this expression by $r_{\pi}$ and recognizing that the product $r_{\pi} g_{m}$ is $\beta_{F}$, we find that we can also write this as

$$
\begin{equation*}
A_{v}=-\frac{\beta_{F} R_{L}^{\prime}}{r_{\pi}+\left(\beta_{F}+1\right) R_{E 1}} \tag{11.36b}
\end{equation*}
$$

If $\beta_{F}$ is large, as is typically the case, the $r_{\pi}$ factor in the denominator will be negligible and Eq. (11.36b) for $A_{v}$ can be simplified significantly to

$$
\begin{equation*}
A_{\nu} \approx-\frac{R_{L}^{\prime}}{R_{E 1}} \tag{11.36c}
\end{equation*}
$$

We now see that $A_{\nu}$ depends only on the ratio of resistor values. This is a useful result for an integrated circuit amplifier because it is often difficult to fabricate integrated circuit resistors to within 20 percent of their design value; however, the ratio of resistor values can easily be maintained to within a few percent of a
*This discussion can readily be quantified; this is done in Sec. 13.3. You may want to look ahead to that section and particularly to Fig. 13.17, which should help you visualize the concept of feedback stabilization.


FIGURE 11.8
Degenerate-emitter stage: (a) the full circuit; (b) the small-signal linear equivalent circuit for mid-band analysis.
design value. The temperature dependence of $A_{v}$ is, of course, also completely removed, assuming the temperatures of the two resistors stay the same.

Comparing Eq. (11.36c) with Eq. (11.21), we see that the magnitude of the gain is now smaller by a factor of essentially $1 /\left(g_{m} R_{E 1}\right)$, which can also be written as $r_{\pi} / \beta_{F} R_{E 1}$. We said earlier that $r_{\pi}$ is much smaller than $\beta_{F} R_{E 1}$, so clearly this factor is much less than 1 . This reduction in the magnitude of the voltage gain is one of the costs we must pay for the increased control that we have achieved over the value of the voltage gain.

The magnitude of the current gain is also reduced significantly from that of the common-emitter circuit. A little algebra shows that it is approximately

$$
\begin{equation*}
A_{i} \approx-\frac{R_{C}}{R_{C}+R_{L}} \cdot\left(\frac{R_{B}^{\prime}}{R_{E 1}}\right) \tag{11.37}
\end{equation*}
$$

The parameter $\beta$ does not enter this expression for the current gain, as long as $\beta$ is large, but again a price has been paid for increased control and stability. The first factor in Eq. (11.37) is typically of order $\frac{1}{2}$, whereas the second factor might be as large as 30 , yielding a current gain of 10 to 15 , rather than $\beta_{F}$ as in the common-emitter circuit.

The mid-band power gain is easily found as the product of Eqs. (11.36c) and (11.37). It is maximum when $R_{C}=R_{L}$, as expected, and is given approximately by

$$
\begin{equation*}
A_{p, \max } \approx \frac{R_{L} R_{B}^{\prime}}{4 R_{E 1}^{2}} \tag{11.38}
\end{equation*}
$$

The output resistance of this stage is the same as that of a common-emitter amplifier (i.e., $R_{C}$ ), but the input resistance is now significantly larger and is one of the important characteristics of this circuit. The input resistance is now essentially $(\beta+1) R_{E 1}$, in parallel with $R_{B}^{\prime}$. To see this we first write

$$
\begin{equation*}
R_{\mathrm{in}}=R_{B}^{\prime} \| \frac{1+R_{E 1}\left(g_{m}+g_{\pi}\right)}{g_{\pi}} \tag{11.39a}
\end{equation*}
$$

or, equivalently,

$$
\begin{equation*}
R_{\mathrm{in}} \approx R_{B}^{\prime} \|\left[\left(\beta_{F}+1\right) R_{E 1}+r_{\pi}\right] \tag{11.39b}
\end{equation*}
$$

If we approximate $\left(\beta_{F}+1\right)$ as $\beta_{F}$ and neglect $r_{\pi}$ relative to the other terms, this becomes

$$
\begin{equation*}
R_{\mathrm{in}} \approx R_{B}^{\prime} \| \beta_{F} R_{E 1} \tag{11.39c}
\end{equation*}
$$

Usually this is essentially $R_{B}^{\prime}$ because $\beta_{F} R_{E 1}$ is very much the larger factor. In this case we would want to make the base bias resistors, $R_{B 1}$ and $R_{B 2}$, as large as possible, keeping in mind the desirability of having the quiescent bias current through them be much larger than the quiescent transistor base current $I_{B}$.

## Example

Question. Consider a circuit identical to the one in the preceding example except that the entire emitter resistor is no longer shorted incrementally to ground. Assume that the circuit now looks like that in Fig. $11.8 a$ with $R_{E 1}=0.5 \mathrm{k} \Omega$ and $R_{E 2}=$ $2.0 \mathrm{k} \Omega$. What are $A_{v}, A_{i}, A_{p}$, and $R_{\mathrm{in}}$ in this circuit?

Discussion. The product $g_{m} R_{E 1}$ is 20 , which allows us to use Eq. (11.36c) for $A_{\nu}$. Doing this we find that $A_{v}$ is -3 . We also find that $A_{i}$ is now -13.65 and $A_{p}$ is +41 . These gains are considerably smaller than the corresponding quantities for a common-emitter amplifier.

The input resistance is $\left[(\beta+1) R_{E 1}+r_{\pi}\right]$, which is $39.7 \mathrm{k} \Omega$, in parallel with $R_{B}^{\prime}$, which is $13.7 \mathrm{k} \Omega$; the combination is $10.2 \mathrm{k} \Omega$, which is clearly dominated by $R_{B}^{\prime}$. A high input resistance is one of the attractive features of this stage.

The degenerate-emitter stage might seem like a good place to use a nonlinear active load as a way to recover the gain we lose from the presence of $R_{E 1}$,
but this is not often done. If emitter degeneracy is being used to increase the input resistance, then using it with an active load makes sense, but if it is being used to accurately set the gain (as is more common), an active load is counterproductive. This is because the effective resistance of a nonlinear active load is not a well-controlled parameter; therefore its value can be expected to vary widely from circuit to circuit. Consequently the advantage of using emitter degeneracy to precisely set the gain of the stage is lost.

We should point out that the use of emitter degeneracy is a form of feedback. An element such as $R_{E 1}$ (which appears in both the input and the output circuit) couples, or feeds back, some of the output signal to the input of the transistor in such a way that it controls the gain more precisely, albeit at a lower magnitude.

The degenerate-emitter amplifier stage may be summarized as follows: the use of a feedback resistor in the emitter yields a high input resistance and midband gains that depend only on the ratios of resistor values in the circuit and are independent of the transistor parameters.

### 11.3.3 Common-Base Stage

Sometimes we need an amplifier stage that has a very small input resistance, even smaller than that available from a common-emitter amplifier. This can be achieved by applying the input signal to the emitter of a bipolar transistor, taking the output off the collector, and incrementally grounding the base. This is illustrated for our standard resistively biased, capacitively coupled circuit topology in Fig. 11.9a. It is more common to draw this circuit, the common-base stage, as shown in Fig. $11.9 b$, which is exactly the same circuit as in Fig. $11.9 a$ with the components positioned differently. The corresponding mid-band small-signal model is presented in Fig. 11.9c.

The mid-band input resistance of this circuit is $R_{E}$ in parallel with $r_{e}$. The resistance $r_{e}$ can be written as $\left(g_{m}+g_{\pi}\right)^{-1}$; writing it this way we can recognize that $r_{e}$ is usually quite small, so that we have

$$
\begin{equation*}
R_{\mathrm{in}}=R_{E} \| r_{e} \approx r_{e}=\frac{1}{g_{m}+g_{\pi}}=\frac{1}{g_{m}\left(1+1 / \beta_{F}\right)} \tag{11.40a}
\end{equation*}
$$

When $\beta_{F}$ is large, we can neglect $1 / \beta_{F}$ relative to 1 and this becomes

$$
\begin{equation*}
R_{\mathrm{in}} \approx \frac{1}{g_{m}}=\frac{r_{\pi}}{\beta_{F}} \tag{11.40b}
\end{equation*}
$$

This is much smaller (by a factor of $\beta_{F}$ ) than the input resistance of the commonemitter stage; it can be on the order of 25 to $50 \Omega$ (see the example below).

The output resistance of the common base circuit is the same as that of the common-emitter and degenerate-emitter circuits. The magnitude of the voltage gain of this circuit is the same as that of the common-emitter circuit, but is now positive:

$$
\begin{equation*}
A_{v}=+g_{m} R_{L}^{\prime} \tag{11.41}
\end{equation*}
$$



FIGURE 11.9
Common-base stage: (a) the full circuit drawn in the format used in earlier figures; (b) the full circuit in more standard common-base format; (c) the small-signal linear equivalent circuit for mid-band analysis.

The current gain is also positive but is now less than 1 :

$$
\begin{equation*}
A_{i} \approx \frac{R_{C}}{R_{C}+R_{L}} \tag{11.42}
\end{equation*}
$$

assuming that the product $R_{E}\left(g_{m}+g_{\pi}\right)$ is much greater than 1 , as is typically the case. The power gain is still greater than 1 , however, and the circuit is a very useful amplifier stage. The maximum power gain, which occurs when $R_{C}=R_{L}$, is approximately

$$
\begin{equation*}
A_{p} \approx \frac{g_{m} R_{L}}{4} \tag{11.43}
\end{equation*}
$$

## Example

Question. Consider a common-base stage biased using the same supply and resistor values used in the preceding examples. What are the mid-band voltage, current, and power gains of this stage, and what is the input resistance?

Discussion. Using Eqs. (11.41) through (11.43), we find that $A_{v}$ is $60, A_{i}$ is 0.5 , and $A_{p}$ is 30 . The input resistance $R_{\text {in }}$ is $25 \Omega$, by far the lowest of any of the stages we have considered thus far.

In summary, the common-base circuit has a very low input resistance, high voltage gain, and no net current gain. It is a useful first stage in applications where a low input resistance is important.

### 11.3.4 Emitter-Follower Stage

All of the stages we have looked at thus far have had the same relatively large output resistance $R_{C}$. A stage with a low output resistance can be obtained by putting the input on the base, taking the output off the emitter, and making the collector common to both input and output (i.e., incrementally grounding it). This circuit is called the common-collector stage or the emitter-follower stage. It is illustrated in Fig. 11.10a using our standard resistor biasing and capacitor coupling. The mid-band equivalent circuit is illustrated in Fig. 11.10b.

The voltage gain of this stage is given by

$$
\begin{equation*}
A_{\nu}=\frac{1}{1+\left[1 /\left(g_{m}+g_{\pi}\right) R_{L}^{\prime}\right]} \tag{11.44a}
\end{equation*}
$$

where $R_{L}^{\prime}$ is now $R_{E}$ in parallel with $R_{L}$. Since $\left(g_{m}+g_{\pi}\right) R_{L}^{\prime}$ is typically much greater than 1 , this expression for $A_{\nu}$ reduces to approximately 1 , that is,

$$
\begin{equation*}
A_{\nu} \approx 1 \tag{11.44b}
\end{equation*}
$$

Note that $A_{v}$ is in fact very slightly less than 1 . Thus the output very closely matches, or follows, the input. Since the output is taken off the emitter, we arrive at the name emitter-follower.

Although the voltage gain is 1 , the current gain is still appreciable for this stage. The expression is complicated because there are several current dividers in the circuit, but we find that we have approximately


FIGURE 11.10
Emitter-follower stage: ( $a$ ) the full circuit; $(b)$ the small-signal linear equivalent circuit for mid-band analysis.

$$
\begin{equation*}
A_{i} \approx \frac{R_{B}^{\prime}}{R_{L}} \tag{11.45}
\end{equation*}
$$

Emitter-follower stages are designed to have a large input resistance (see below) and to be used with small load resistances, so $A_{i}$ is typically large. Note, finally, that since the voltage gain is approximately 1 , the current and power gains are essentially equal.

The input resistance of the emitter-follower stage is $R_{B}^{\prime}$ in parallel with $(\beta+1) R_{L}^{\prime}$, where $R_{L}^{\prime}$ is the parallel combination of $R_{E}, R_{L}$, and $r_{o}$; that is,

$$
\begin{equation*}
R_{\mathrm{in}} \approx R_{B}^{\prime} \|\left[(\beta+1) R_{L}^{\prime}+r_{\pi}\right] \tag{11.46}
\end{equation*}
$$

This is clearly very much larger than $R_{L}$, and this stage very effectively buffers stages preceding it from small resistance loads, such as audio speakers, etc.

The output resistance of the emitter-follower stage is much lower than any of the other stages we have studied. Looking back in at the output terminals with $v_{t}$ set to zero, we find

$$
\begin{equation*}
R_{\mathrm{out}}=R_{E}\left\|\frac{\left(R_{T} \| R_{B}^{\prime}\right)+r_{\pi}}{\beta+1}\right\| r_{o} \tag{11.47}
\end{equation*}
$$

For typical bias levels, $\left[\left(R_{T} \| R_{B}^{\prime}\right)+r_{\pi}\right] /(\beta+1)$ is by far the smallest of the three parallel resistances in Eq. (11.47), and we have, assuming $\beta$ is much greater than 1 ,

$$
\begin{equation*}
R_{\mathrm{out}} \approx \frac{\left(R_{T} \| R_{B}^{\prime}\right)+r_{\pi}}{\beta} \tag{11.48}
\end{equation*}
$$

The output resistance is clearly much smaller than the output resistance of the input circuit (i.e., than $R_{T}$ alone).

## Example

Question. Consider an emitter-follower stage like that in Fig. 11.10a with $R_{B 1}=$ $39 \mathrm{k} \Omega, R_{B 2}=21 \mathrm{k} \Omega, R_{E}=2.5 \mathrm{k} \Omega, R_{L}=1 \mathrm{k} \Omega$, and $R_{T}=1 \mathrm{k} \Omega$. What are the linear small-signal mid-band voltage, current, and power gains; and what are the input and output resistances of this circuit?

Discussion. $R_{L}^{\prime}$ is $0.71 \mathrm{k} \Omega$, so $\left(g_{m}+g_{\pi}\right) R_{L}^{\prime}$ is approximately 29 and $A_{v}$ is then 0.97 (i.e,, essentially 1 ). The current and power gains are approximately 14 . The input resistance is essentially $R_{B}^{\prime}$, and the output resistance is just under $40 \Omega$. This $R_{\text {out }}$ is far smaller than in any of the preceding stages.

In summary, the emitter-follower is characterized by a large input resistance, small output resistance, unity voltage gain, and modest current and power gains.

### 11.4 SINGLE FIELD EFFECT TRANSISTOR AMPLIFIERS

We will continue to use $n$-channel, enhancement mode metal-oxide-semiconductor field effect transistors, or MOSFETs, for purposes of illustration as we now extend our discussion of single-transistor amplifiers to include field effect transistors. The results we obtain will, however, be applicable to all types of field effect transistors.

There are many similarities between the small-signal analysis and performance of bipolar and field effect transistor circuits, and we can use our knowledge of bipolar transistor circuits in our analysis to take certain shortcuts. The circuits we will consider-the common-source, degenerate-source, common-gate, and source-follower circuits-are the FET analogs to the common-emitter, degenerateemitter, common-base, and emitter-follower bipolar circuits, respectively. The FET and bipolar circuits share many properties. You will notice, however, some important differences that arise from the fact that the input resistance of a field
effect transistor is extremely large. A large input resistance is one of the attractive features of FETs.

### 11.4.1 Common-Source Stage

As we did when we discussed common-emitter amplifiers, we will divide our discussion of common-source amplifiers into two parts. The first deals with circuits that have only linear resistors as load elements in the drain circuit, and the second deals with the use of nonlinear, active elements as loads. We will see that using nonlinear active loads is much more important in FET amplifier design than it is in bipolar design and makes possible some very exciting circuits.
a) Linear-resistor load. A capacitively coupled, resistively biased commonsource field effect transistor circuit is shown in Fig. 11.11a. In this circuit a voltage divider is used to set the gate-to-source bias, which then fixes the drain current as satisfying

$$
\begin{equation*}
I_{D}=\frac{K}{2}\left(\frac{R_{G 2} V_{D D}}{R_{G 1}+R_{G 2}}-I_{D} R_{S}-V_{T}\right)^{2} \tag{11.49}
\end{equation*}
$$

The mid-band incremental equivalent circuit for the common-source amplifier of Fig. $11.11 a$ is shown in Fig. 11.11b. The resistance $R_{G}^{\prime}$ is $R_{G 1}$ in parallel with $R_{G 2} . R_{L}^{\prime}$ is the parallel combination of $r_{o}, R_{D}$, and $R_{L}$.*

Looking first at the mid-band voltage gain $A_{\nu}$, we see from Fig. 11.11 $b$ that $v_{\text {out }}$ is $-g_{m} v_{g s} R_{L}^{\prime}$ and that $v_{g s}$ is $v_{\text {in }}$, so we immediately have

$$
\begin{equation*}
A_{v}=-g_{m} R_{L}^{\prime} \tag{11.50}
\end{equation*}
$$

This voltage gain has its maximum possible value for a given transistor when $R_{L}$ and $R_{D}$ are much larger than $r_{o}$, in which case

$$
\begin{equation*}
A_{v}=A_{v, \max } \equiv-g_{m} r_{o}=-\frac{g_{m}}{g_{o}} \tag{11.51a}
\end{equation*}
$$

This quantity is very much dependent on the bias point because both $g_{m}$ and $r_{o}$ depend on the quiescent drain current. That is, $g_{m}$ is $\sqrt{2 K\left|I_{D}\right|}$ and $r_{o}$ is $\left|V_{A}\right| / I_{D}$, where $V_{A}$ is the Early voltage of the transistor. Thus

$$
\begin{equation*}
A_{v, \max }=-\left|V_{A}\right| \sqrt{\frac{2 K}{\left|I_{D}\right|}} \tag{11.51b}
\end{equation*}
$$

This expression tells us immediately that to make $A_{v, \max }$ large we want to keep the quiescent drain current small.

[^14]
(a)

(b)

(c)

FIGURE 11.11
(a) Common-source amplifier circuit; (b) its mid-band small-signal linear equivalent circuit; (c) a second common-source amplifier circuit biased in such a way as to achieve an infinite mid-band input resistance (doing this requires the use of two bias supplies, $V_{D D}$ and $V_{S S}$ ).

Another useful form for $A_{\nu, \text { max }}$ can be obtained by writing $I_{D}$ in saturation as $K\left(V_{G S}-V_{T}\right)^{2} / 2$, which yields

$$
\begin{equation*}
A_{\nu, \max }=-\frac{2\left|V_{A}\right|}{\left|V_{G S}-V_{T}\right|} \tag{11.51c}
\end{equation*}
$$

As a practical matter, it is difficult to bias an FET within several $k T / q$ of $V_{T}$, so the factor $\left|V_{G S}-V_{T}\right|$ will typically be 4 to $5 \mathrm{kT} / \mathrm{q}$. This fact, coupled with the fact that $\left|V_{A}\right|$ for MOSFETs tends to be less than for BJTs, results in $A_{\nu, \text { max }}$ for a typical MOSFET being as much as an order of magnitude (i.e., 10 times) smaller than that of a typical BJT.

Unfortunately, as we discussed at length in Sec. 11.3.1a, we cannot realize a voltage gain of $A_{\nu, \text { max }}$ in a stage biased through a linear output resistor because we cannot make $R_{D}$ arbitrarily large and keep the transistor biased in its forward active region. Using the same arguments we used in Sec. 11.3.1a, we can show that to have $R_{D}$ larger than $r_{0}$ we must have the maximum voltage drop across $R_{D}$, which we can call $V_{D, \mathrm{MAX}}$, larger than $\left|V_{A}\right|$, and this is not a likely situation. It is only with active nonlinear loads, which we will discuss in the next subsection, that we can hope to approach $A_{v, \max }$.

In most situations where $R_{D}$ is a linear resistor and the transistor has a reasonable Early voltage, $r_{0}$ will be greater than $R_{D}$. In addition, $r_{o}$ can frequently be neglected compared to $R_{D}$ and $R_{L}$. In this case, the voltage gain becomes

$$
\begin{equation*}
A_{v} \approx-\frac{g_{m} R_{L} R_{D}}{R_{D}+R_{L}} \tag{11.52a}
\end{equation*}
$$

To understand what freedom we have to make this factor large, it is helpful to write $g_{m}$ in terms of its bias point dependence:

$$
\begin{equation*}
A_{\nu}=-\sqrt{2 K I_{D}} \frac{R_{L} R_{D}}{R_{D}+R_{L}} \tag{11.52b}
\end{equation*}
$$

As we have just said, the voltage drop $I_{D} R_{D}$ across resistor $R_{D}$ can only be so large or the MOSFET will no longer be in saturation; this has important implications for the voltage gain in this case. Writing $A_{v}$ to isolate this product, we have

$$
\begin{equation*}
A_{\nu}=-\sqrt{\frac{2 K}{I_{D}}} I_{D} R_{D} \frac{R_{L}}{R_{D}+R_{L}} \tag{11.52c}
\end{equation*}
$$

Written this way, we can see that the prescription for maximizing the voltage gain of a common-source stage is to use a transistor with the largest available value for $K$ and to keep the $I_{D} R_{D}$ product as large as possible. Within this later constraint we also want to keep $I_{D}$ as small as possible. Doing this implies that $R_{D}$ must be made larger, which will eventually make the last term in Eq. (11.52c) smaller, but in a MOSFET circuit it is often the case that $R_{L}$ is extremely large (it may even be infinite), and so $R_{D}$ can usually be made quite big before it starts to have a detrimental effect on the gain.

Next consider the mid-band current gain $A_{i}$ of this stage. The output current $i_{\text {out }}$ is the fraction of $-g_{m} v_{g s}$ flowing through $R_{L}$, which, neglecting $r_{o}$,
is $-g_{m} v_{g s} R_{D} /\left(R_{L}+R_{D}\right)$; and $v_{g s}$ is $i_{\text {in }} R_{G}^{\prime}$. Combining these and dividing by $i_{\text {in }}$ yields

$$
\begin{equation*}
A_{i}=-\frac{g_{m} R_{G}^{\prime} R_{D}}{R_{D}+R_{L}} \tag{11.53}
\end{equation*}
$$

Finally, multiplying Eqs. (11.52c) and (11.53), we arrive at the mid-band power gain $A_{p}$ :

$$
\begin{equation*}
A_{p}=\frac{g_{m}^{2} R_{G}^{\prime} R_{L} R_{D}^{2}}{\left(R_{D}+R_{L}\right)^{2}} \tag{11.54}
\end{equation*}
$$

The input resistance to this stage is $R_{G}^{\prime}$, and it is important to note that this factor can be much larger for an FET amplifier than is usually the case for a bipolar transistor amplifier. The intrinsic input resistance of a MOSFET is infinite, so the input resistance of the stage is finite only because of the bias resistors, $R_{G 1}$ and $R_{G 2}$. Furthermore, since there is no quiescent gate current, we do not have the same type of limit on how large $R_{G 1}$ and $R_{G 2}$ can be as we do with base bias resistors in a bipolar circuit. The only limit is that we do have to supply charge to the gate capacitor through them, so they cannot truly be infinite; as a practical matter they might be several megaohms.

If we want a larger input resistance, we must use the bias scheme that was shown in Fig. $11.3 b$; a common-source amplifier biased in this way is illustrated in Fig. 11.11c. This circuit requires that we use a second bias supply voltage, but it achieves the maximum input resistance. It also eliminates the input coupling capacitor, which is also good. Before leaving this bias scheme, it is worthwhile to consider how to design it to achieve a particular $I_{D}$. At first glance this seems to be a bit messy because $I_{D}$ is the solution to the quadratic

$$
\begin{equation*}
I_{D}=\frac{K}{2}\left(V_{S S}-I_{D} R_{S}-V_{T}\right)^{2} \tag{11.55}
\end{equation*}
$$

which we obtained by replacing $V_{G S}$ in the expression for $I_{D}$ of a MOSFET in saturation with $V_{S S}-I_{D} R_{S}$. Recall, however, that if you are designing a circuit to achieve a specific bias point, $I_{D}$ is already known; what you need to calculate is either the value of the resistor $R_{S}$ or the bias supply $V_{S S}$. Either of these is a relatively simple calculation given $I_{D}$.

Notice that $A_{i}$ and $A_{p}$ are infinite for the circuit in Fig. 11.11c, in which $R_{G}^{\prime}$ is infinite. This observation is a direct result of the infinite input resistance of FETs. In many FET circuits the mid-band current and power gain are infinite, as we have found here.

The output resistance of both of these circuits is $R_{D}$.

## Example

Question. Consider a MOSFET, for which $V_{T}$ is 0.9 V and $K$ is $1 \mathrm{~mA} / \mathrm{V}^{2}$, used in the common-source circuit of Fig. $11.11 b$ with $V_{D D}=5 \mathrm{~V}, V_{S S}=-5 \mathrm{~V}, R_{D}=$ $3 \mathrm{k} \Omega, R_{S}=2.7 \mathrm{k} \Omega$, and $R_{L}=3 \mathrm{k} \Omega$. What is the mid-band linear small-signal voltage gain of this circuit?

Discussion. The bias circuit and device are the same as, the ones we discussed in the example in Sec. 11.1.2, so we know that $I_{D}$ is 1 mA . From Eq. ( 10.42 b ) we then find that $g_{m}$ is 1.4 mS . Thus from Eq. (11.52a), $A_{v}$ is 2.1. This low value reflects the relatively small transconductance. The input resistance is infinite (and, thus, so too are the current and power gains); the output resistance of this stage is $3 \mathrm{k} \Omega$.
b) Nonlinear and active loads. The use of FETs as active loads is very important in FET amplifier design because much more can be gained by using an active load in a FET amplifier than can be gained in a bipolar amplifier. This is true, as we shall see, in large part because the input resistance of an FET amplifier stage can be very large, often much larger than that of a bipolar amplifier gain stage, such as a common-emitter stage. A common-source stage like that in Fig. $11.11 b$, for example, ideally has an infinite input resistance, whereas the commonemitter stage in Fig. $11.4 a$ has an input resistance of only a few kilo-ohms. We are typically interested in coupling several single-transistor amplifier stages together to form a multistage amplifier, as we shall see in Chap. 13; in this type of arrangement, the input resistance of one stage is the $R_{L}$ of the preceding stage. In a bipolar circuit, $R_{\text {in }}$ tends to be small (typically a few kilo-ohms) and making $R_{C}$ large increases $R_{L}^{\prime}$ from something on the order of $R_{\text {in }} / 2$ to roughly $R_{\text {in }}$ (i.e., by a factor of 2) at best. With FET stages, on the other hand, $R_{\mathrm{in}}$ can be infinite and the net load resistance $-R_{L}^{\prime}$ in our previous discussions-is now entirely $R_{C}$. Using an active load to make $R_{C}$ big is thus very attractive in this situation because increasing $R_{C}$ by a factor of 10 or 100 will increase $R_{L}^{\prime}$ by the same factor. The payoff is much greater.*

In an integrated circuit based on $n$-channel enhancement mode MOSFETs, a logical first choice for an active load would be another enhancement mode MOSFET. A second choice would be an $n$-channel depletion mode MOSFET. Beyond that, we might consider using a $p$-channel MOSFET or even a pnp bipolar junction transistor, but these require much more complicated processing and have to be worth the trouble. To begin to understand which of these choices are worth the trouble, let us next consider what each of these possible FET loads looks like as a load. (We already know what the BJT looks like from the discussion in Sec. 11.3.1 $b$ and Fig. 11.7.)

Four possible MOSFET loads for an $n$-channel MOSFET amplifier stage are illustrated in Fig. 11.12a through $d$. The depletion mode device is already on, and its gate can simply be shorted to its source as in Fig. 11.12c. Enhancement mode devices, on the other hand, are normally off, and a voltage needs to be applied to their gates to turn them on so that they conduct and function as a finite load. The most desirable way to do this is to apply a bias between the gate

[^15]

FIGURE 11.12
Four possible diode connections of MOSFETs that are useful as loads in an $n$-channel enhancement mode MOSFET amplifier circuit: (a) an enhancement mode $n$-channel MOSFET biased in saturation with $v_{G S}=\nu_{D S} ;(b)$ an enhancement mode $n$-channel MOSFET biased in its linear region; ( $c$ ) a depletion mode $n$-channel MOSFET with $v_{G S}=0 \mathrm{~V}$; (d) a $p$-channel enhancement mode MOSFET; (e) the large-signal diode characteristics of each connection. In plotting these characteristics it was assumed for circuit (a) that $K=0.16 \mathrm{~mA} / \mathrm{V}^{2}$ and $V_{T}=1 \mathrm{~V}$; for $(b)$ that $K=28 \mu \mathrm{~A} / \mathrm{V}^{2}, V_{T}=1 \mathrm{~V}$, and $V_{\mathrm{REF}}=10 \mathrm{~V}$; for $(c)$ that $K=1 \mathrm{~mA} / \mathrm{V}^{2}$ and $V_{T}=-2 \mathrm{~V}$; and for $(d)$ that $K=1 \mathrm{~mA} / \mathrm{V}^{2}, V_{T}=-1 \mathrm{~V}$, and $V_{\text {REF }}=3 \mathrm{~V}$. The characteristic of a linear resistor is shown as a dashed line for comparison.
and source, as is done for the $p$-channel MOSFET load in Fig. 11.12d; but doing this turns out to be impractical when using an $n$-channel MOSFET as a load with an $n$-channel amplifier MOSFET, so the bias must be applied between the drain and gate, as is seen in Figs. $11.12 a$ and $b$.

There are several ways in which we can view these loads. One is to look at their large-signal characteristics in the connections shown. Realizing that the slope of the characteristic at any point is the incremental conductance of the load at that bias point, we see that the flatter the curve, the lower the conductance and the higher the resistance. The large-signal terminal characteristics of each of the
connections are plotted in Fig. 11.12e. Looking at these characteristics it is clear that the first two options (i.e., those that involve using an enhancement mode $n$ channel device) present lower incremental resistances than do the other two over much of their ranges. Thus they are not such attractive options for analog amplifier applications. The last two options, which involve using either a depletion mode $n$-channel MOSFET or an enhancement mode $p$-channel device, can have much higher resistances and are much more attractive. In fact, based on the large-signal characteristics, which were derived using our basic large-signal model for the MOSFET, we might think that the incremental resistance of these connections can be infinite if they are biased properly; that is, the characteristics look flat when the transistors are saturated, but we know they are not. The problem, of course, is that our basic large-signal model neglects channel length modulation (the Early effect) and body effects. Both of these effects are included in our incremental model, however, and it is easy for us to use that model to evaluate the incremental behavior of each connection. We will do this now, looking at each of the four connections in turn.

Enhancement mode MOSFET. An inverter stage loaded with the MOSFET diode connection in Fig. $11.12 a$ is shown in Fig. 11.13a. Notice that to turn this device "on" it is necessary to connect its gate to the drain, making $v_{G S L}$ equal to $v_{D S L}$.* Thus the device is clearly always saturated as long as $v_{D S L}$ is greater than $V_{T L}$, since $v_{D S L}$ is automatically larger than $\left(v_{G S L}-V_{T L}\right)$. [If $v_{D S L}\left(=v_{G S L}\right)$ is less than $V_{T L}$, the device is no longer "on."] In this case the load MOSFET looks incrementally like a resistor of magnitude $1 / g_{m L}$. How this comes about is illustrated in Fig. 11.13b. As shown in (i), the gate and drain are connected together; thus, as shown in (ii), $v_{g s}=v_{d s}$ and the dependent current generator $g_{m} v_{g s}$ can also be written as $g_{m} v_{d s}$. Electrically this is equivalent to having a conductance of magnitude $g_{m}$ in parallel with $g_{0}$ between the drain and source; this is shown in (iii). In most devices, $g_{m}$ will be much larger than $g_{o}$ and we arrive at our result: the load looks like a resistor of magnitude $1 / g_{m L}$. In the present situation $g_{m L}$ is $K_{L}\left(V_{D D}-V_{\text {OUT }}-V_{T L}\right)$ since $v_{G S L}$ is $\left(V_{D D}-V_{O U T}\right)$; the incremental equivalent circuit is as shown in Fig. 11.13c. Unfortunately, however, this incremental load resistance is less than the static resistance $V_{D S L} / I_{D L}$ by a factor of $\left(V_{D D}-V_{\text {OUT }}-V_{T L}\right) / 2\left(V_{D D}-V_{O U T}\right)$. To see this we simply use the fact that $V_{D S L}$ is $\left(V_{D D}-V_{O U T}\right)$ and $I_{D L}$ is $K_{L}\left(V_{D D}-V_{\text {OUT }}-V_{T L}\right)^{2} / 2$ and compare their ratio to $1 / g_{m L}$. Since the active load resistance is lower, we are better off (at least in this case) using a linear resistor!

A partial solution to this problem is to connect the gate to a third supply, $V_{G G}$, as shown in Fig. 11.14a, and to force the load FET into its linear region. Now the load MOSFET again looks incrementally like $g_{m L}$ in parallel with $g_{o L}$

[^16]

FIGURE 11.13
Use of a saturated enhancement mode MOSFET as the load in a common-source amplifier stage: (a) the complete stage; (b) (i) the load connection, (ii) the small-signal equivalent circuit, and (iii) the effective equivalent circuit forming the load; (c) the incremental equivalent circuit of the stage.


FIGURE 11.14
Use of an enhancement mode MOSFET strongly biased in its linear region as the load in a common-source amplifier stage: (a) the entire circuit; (b) (i) the load connection, (ii) the small-signal equivalent circuit, and (iii) the effective equivalent circuit forming the load; (c) the incremental equivalent circuit of the entire stage.
(as Fig. $11.14 b$ shows), but now $g_{m L}$ is smaller than before. This load looks very much like a linear resistor as $V_{G G}$ is made very large. Nonetheless, an enhancement mode load is never any better than using a linear resistor. Having to provide another voltage supply is also a major complication-not so much because it has to supply much current (it is, after all, connected only to MOSFET gates) but rather because it has to be wired to all those gates. The only advantage that using this circuit might have over using a simple resistor load is that a MOSFET occupies less area in an integrated circuit layout than a resistor.

Depletion mode MOSFET ( $n$-MOS). A far better active load is an $n$-channel depletion mode MOSFET. If we are making an integrated circuit, we presumably already have enhancement mode FETs in our process, and it turns out that simultaneously making depletion mode FETs is not particularly difficult or costly. The resulting circuit is shown in Fig. 11.15a, and the incremental equivalent circuits for the load device and the entire stage are shown in Figs. $11.15 b$ and $c$, respectively.

There are several important new features in the circuit of Fig. 11.15a that you should note before proceeding. First, notice that it is biased using the scheme of Fig. $11.3 c$, in which a large resistance $R_{G}$ is placed between the drain and gate of the driver transistor to ensure that it is biased in saturation and, equally important, that it is biased at a level of drain current set by the load, which is another saturated FET (i.e., a current source). (The depletion mode load MOSFET is saturated as long as $V_{D D}-v_{\text {OUT }}$ is greater than the magnitude of the threshold of the load MOSFET.) With two current sources in series, as we have here, we are asking for trouble unless the current in one depends on the current in the other in some way; the use of $R_{G}$ to bias the driver so that it tracks the load is a very convenient solution to this problem. It is certainly much simpler than the arrangement that had to be used in the analogous bipolar circuit in Fig. 11.5. It is not without its cost, however, as you will explore in the problems in this chapter and Chap. 14. In our static analysis we can let $R_{G}$ be arbitrarily large so that any problems disappear.

The second thing to notice about the circuit of Fig. $11.15 a$ is that the substrate terminal of the load FET is not connected to the source as it was in Figs. 11.11 through 11.14; instead, it is grounded. This is more realistic because it represents the situation in an integrated circuit where all of the devices share a common substrate that is incrementally grounded. Thus the substrate generator $g_{m b L}$ should be included as it is in Fig. 11.15b. Strictly speaking, we should also have done this in Figs 11.11 through 11.14, but doing so there would not have changed our results significantly. Now, the situation is very different. The incremental load resistance is now $1 /\left(g_{m b L}+g_{o L}\right)$, as Fig. $11.15 c$ shows, and if the bias is such that the load FET is saturated, $g_{m b L}$ will dominate this expression and the small-signal voltage gain of the stage will be approximately $g_{m D} / g_{m b L}$. This is much larger than we could achieve with a linear resistor load, but it is less than if $v_{b s L}$ were zero and the substrate generator did not play a role.


## FIGURE 11.15

Use of a saturated depletion mode MOSFET as the load in a common-source amplifier stage: (a) the complete stage; (b) (i) the load connection, (ii) the small-signal equivalent circuit, and (iii) the effective equivalent circuit forming the load; (c) the incremental equivalent circuit of the entire stage. We assume that $R_{G}$ can be made arbitratily large and subsequently neglected in the incremental circuit.

It is instructive to look at the gain expression further by using our expressions for the model parameters in terms of the bias point. We have, assuming no loading from subsequent stages:

$$
\begin{equation*}
A_{v} \cong-\frac{g_{m D}}{g_{m b L}} \tag{11.56a}
\end{equation*}
$$

In terms of the bias point, these conductances are

$$
\begin{equation*}
g_{m D}=\sqrt{2 K_{D} I_{D D}} \tag{11.57a}
\end{equation*}
$$

and

$$
\begin{equation*}
g_{m b L} \equiv \eta g_{m D}=\eta \sqrt{2 K_{L} I_{D L}} \tag{11.57b}
\end{equation*}
$$

Combining all of these results and noting also that $I_{D L}$ and $I_{D D}$ are equal, we have

$$
\begin{equation*}
A_{\nu} \cong-\frac{1}{\eta} \sqrt{\frac{K_{D}}{K_{L}}} \tag{11.56b}
\end{equation*}
$$

Finally, recalling that $K$ is $(W / L) \mu_{e}\left(\varepsilon_{\mathrm{ox}} / t_{\mathrm{ox}}\right)$, we see that this can be written as

$$
\begin{equation*}
A_{v} \simeq-\frac{1}{\eta} \sqrt{\frac{W_{D}}{W_{L}} \frac{L_{L}}{L_{D}}} \tag{11.56c}
\end{equation*}
$$

We see from this equation that the gain of this stage depends not on the bias current (as long as the MOSFETs are biased in saturation) but rather on the MOSFET dimensions and the factor $\eta$. With regard to the dimensions, it is clear that to get the largest possible voltage gain we want the driver device to be wide and short and the load device to be narrow and long.

Complementary MOSFET (CMOS). To eliminate the substrate generator and obtain the highest possible gain from a MOSFET amplifier stage, we need to be able to separate the substrates of the load and driver devices. A particularly elegant way to do this in an integrated circuit is to use a $p$-channel device for the load of an $n$-channel driver as is shown in Fig. 11.16a. For this to work, this circuit must be made perfectly symmetrical in the sense that $Q_{3}$ is identical to $Q_{4}$, $Q_{1}$ to $Q_{2}$, and $R_{S 1}$ to $R_{S 2}$. Because this circuit involves both $n$ - and $p$-channel devices, it is called a complementary MOS, or CMOS, circuit.

In CMOS circuits, the $p$-type substrate region of the $n$-channel device is isolated from the $n$-type substrate region of the $p$-channel device by the $p-n$ junction at their interface as illustrated in Fig. 11.17. This junction is reversebiased because, as the circuit illustrates, the $p$-type substrate of the $n$-channel device is connected to either ground or a negative voltage supply $V_{S S}$, and the $n$ type substrate of the $n$-channel device is connected to the positive voltage supply $V_{D D}$. The processing required to fabricate both $n$ - and $p$-channel devices on the same silicon wafer is complicated, but the technology to do so has been thoroughly developed for digital integrated circuits, where CMOS technology also has major advantages over other technologies, as we shall see in Chap. 15. Thus, although the processing is more complicated, it is economical to use CMOS circuits in linear circuit design.


FIGURE 11.16
Use of a p-channel enhancement mode MOSFET biased in saturation as the load in a common-source amplifier stage with an $n$-channel driver-the basic complementary MOS (CMOS) amplifier stage: (a) the entire circuit; (b) (i) the load connection, (ii) the small-signal equivalent circuit; and (iii) the effective equivalent circuit forming the load; (c) the incremental equivalent circuit of the entire stage.


FIGURE 11.17
Cross-sectional drawing of a complementary MOS integrated circuit, illustrating how a $p$-type "substrate region" is formed in an otherwise $n$-type wafer and showing that there is a $p-n$ junction formed between the $n$-and $p$-type regions. Other examples of CMOS structures are to be found in App. G.

The fact that the substrate and source of the load FET in the CMOS circuit are connected means that the load looks simply like the $g_{0}$ of the load FET in parallel with the $g_{o}$ of the driver device, as is illustrated in Fig. 11.16c. The load device is biased into saturation to maximize its output resistance using a scheme analogous to that used when a pnp bipolar transistor was used as a load for an $n p n$ common-emitter stage in Fig. 11.7b. As was the case there, this type of load is usually implemented in a differential amplifier context rather than a single-transistor amplifier context, and is then called a current mirror. (We will study differential amplifiers in Chap. 12 and current mirrors in Chap. 13.) CMOS amplifiers like this can have very high gains, as we shall see next, and are very important in integrated amplifier design.

Looking further at the gain of this stage, we have, assuming no loading from the following stage (i.e., $R_{L}$ infinite),

$$
\begin{equation*}
A_{v}=\frac{g_{m}}{g_{o D}+g_{o L}} \tag{11.58a}
\end{equation*}
$$

With this result we see that at last we are approaching the maximum possible common-source voltage gain $A_{v, \text { max }}$ given in Eq. (11.51a).

Writing the output conductances in terms of the Early voltages and $I_{D}$, and writing the transconductance in terms of $I_{D}$, we can study the bias dependence of this gain. We have

$$
\begin{equation*}
A_{v}=\frac{\sqrt{2 K_{D} I_{D}}}{I_{D}\left[\left(1 / V_{A D}\right)+\left(1 / V_{A L}\right)\right]}=\sqrt{\frac{2 K_{D}}{I_{D}}} \frac{V_{A D} V_{A L}}{V_{A D}+V_{A L}} \tag{11.58b}
\end{equation*}
$$

Looking at this expression we see that there are very few design decisions that need to be made to make a high-gain CMOS amplifier. Clearly we want a large $K_{D}$ and large Early voltages, and beyond that we simply want to make the drain current as small as practical.

A word of caution is in order at this point concerning the circuit in Fig. $11.16 a$. This circuit relies heavily on exact matching of the components (i.e., $Q_{1}$
and $Q_{2}, Q_{3}$ and $Q_{4}$, and $R_{S 1}$ and $R_{S 2}$ ). Thus it is practical only in an integrated circuit context where all of the elements are fabricated simultaneously and are thus very closely matched. Even then the bias is unlikely to be stable and in the forward active region unless the amplifier is used in a feedback loop. This is the same type of problem we discussed for high-gain bipolar amplifiers in Sec. $11.3 .1 b$ and is familiar to you from working with operational amplifiers. Our objective in making a very high-gain amplifier, after all, is generally not to use all of that gain directly, but rather to use that gain in a feedback loop. Doing this we can make an amplifier that depends not on the actual value of the gain of the high-gain element but rather on the ratio of resistor values, and is thus very stable and highly predictable. We also can make many other circuits this way that are useful in signal processing applications (i.e., multipliers, adders, etc.), circuits you are familiar with from your work with generic operational amplifiers.

### 11.4.2 Degenerate-source

The sensitivity of an FET amplifier to the specific device characteristics and to the bias point can be reduced by using feedback, just as was possible with bipolar

(a)

(b)

FIGURE 11.18
(a) Degenerate-source amplifier; (b) the mid-band small-signal linear equivalent circuit.
transistor amplifiers by using emitter degeneracy. Here the analogous solution is source degeneracy. A resistively biased degenerate-source FET amplifier circuit using two bias supplies is illustrated in Fig. 11.18a. The corresponding mid-band linear equivalent small-signal circuit is illustrated in Fig. 11.18b. Notice that we have included an $R_{G}^{\prime}$ in this equivalent circuit to allow for resistor divider biasing as in Fig. 11.11a; $R_{G}^{\prime}$ is, of course, infinite for the circuit in Fig. 11.18a.

Looking at the mid-band circuit, we see that the voltage gain is now given as

$$
\begin{equation*}
A_{\nu}=-\frac{g_{m} R_{L}^{\prime}}{1+g_{m} R_{S}} \tag{11.59a}
\end{equation*}
$$

If $g_{m} R_{S}$ is much greater than 1 , we have

$$
\begin{equation*}
A_{v} \approx-\frac{R_{L}^{\prime}}{R_{S}} \tag{11.59b}
\end{equation*}
$$

In practice, $g_{m}$ is usually smaller in FET circuits than in bipolar transistor circuits, so this may not always be a good approximation.

The input and output resistances are $R_{G}^{\prime}$ and $R_{D}$, respectively, as they are in the common-source circuit. Notice that because the FET input resistance is already infinite, the presence of $R_{S}$ does not increase $R_{\text {in }}$, whereas having a resistor in the emitter circuit of a bipolar transistor amplifier does increase its $R_{\text {in }}$.

### 11.4.3 Common-gate

On occasion it is useful to have a field effect transistor stage with a low input resistance; in such situations a common-gate topology can be used. An example is shown in Fig. 11.19a, and its mid-band small-signal linear equivalent circuit is shown in Fig. 11.19b.

Looking at this circuit we see that the mid-band input resistance $R_{\text {in }}$ is given by

$$
\begin{equation*}
R_{\text {in }}=R_{S} \| \frac{1}{(\eta+1) g_{m}}=\frac{R_{S}}{1+(\eta+1) g_{m} R_{S}} \tag{11.60}
\end{equation*}
$$

(Remember that $\eta$ is $g_{m b} / g_{m}$ and is less than 1.) This is always less than $R_{S}$, and in the limit of the product $(\eta+1) g_{m} R_{S}$ being much greater than $1, R_{\text {in }}$ approaches $1 /(\eta+1) g_{m}$, which will be much less than $R_{S}$. The output resistance $R_{\text {out }}$ of the common-gate circuit is $R_{D}$, as it was in our two earlier FET circuits.

The mid-band voltage gain $A_{v}$ of this stage is large, that is, $(\eta+1) g_{m} R_{L}^{\prime}$, where $R_{L}^{\prime}$ is the parallel combination of $R_{L}$ and $R_{D}$; and the mid-band current gain $A_{i}$ is given by

$$
\begin{equation*}
A_{i}=\frac{(\eta+1) g_{m} R_{S} R_{D}}{\left[1+(\eta+1) g_{m} R_{S}\right]\left(R_{L}+R_{D}\right)} \tag{11.61}
\end{equation*}
$$

This is essentially 1 . Strictly speaking, it is always less than 1 , but it approaches 1 in the limit $g_{m} R_{S} \gg 1$ and $R_{D} \gg R_{L}$, which is typically the case.


FIGURE 11.19
(a) Common-gate amplifier; (b) the mid-band small-signal linear equivalent circuit.

### 11.4.4 Source-follower

The final field effect transistor stage we consider in this chapter, the sourcefollower stage, has a large input resistance but a low output resistance. In that sense it is just like the emitter-follower circuit, and both are used in similar ways in multistage circuits. The circuit is shown in Fig. 11.20a. The mid-band voltage gain of this stage would ideally be 1 , as it is for the emitter-follower. Notice, however, that the source is not grounded, so the substrate generator (back-gating effect) must be included; this places an important limitation on us. Looking at Fig. $11.20 b$, and noting that $v_{g s}=v_{\text {in }}-v_{\text {out }}$, we see that $A_{v}$ is

$$
\begin{equation*}
A_{v}=\frac{1}{1+\left(g_{m b}+G_{S}+G_{L}\right) / g_{m}} \tag{11.62a}
\end{equation*}
$$

Using the relationship $g_{m b}=\eta g_{m}$, this becomes

$$
\begin{equation*}
A_{v}=\frac{1}{1+\eta+\left(G_{S}+G_{L}\right) / g_{m}} \approx \frac{1}{1+\eta} \tag{11.62b}
\end{equation*}
$$



FIGURE 11.20
(a) Source-follower amplifier; (b) the mid-band linear equivalent circuit. Note that since $v_{b s}=v_{d s}$, the substrate generator factor $g_{m b}$ enters in parallel with $g_{o}$. Notice also that $v_{g s}=\nu_{\text {in }}-v_{\text {out }}$.

We can expect $R_{L}$ and $R_{S}$ to be large, so that the factor $\left(G_{S}+G_{L}\right) / g_{m}$ is much less than 1 , in which case the voltage gain is approximately $1 /(1+\eta)$. Recalling that $\eta$ might be as large as a few tenths, it is easy to see the negative impact that the back-gating effect has on $A_{\nu}$. The back-gating effect can be eliminated by fabricating the $n$-channel MOSFET in a $p$-well (see Fig. 11.17, p. 359), so the back gate can be connected to the source and $v_{B S}$ made zero.

The mid-band input resistance of this stage is infinite, but the output resistance $R_{\text {out }}$ is small. A little consideration shows that $R_{\text {out }}$ is given by

$$
\begin{equation*}
R_{\mathrm{out}}=\frac{1}{g_{m}+g_{m b}+g_{o}+G_{S}} \approx \frac{1}{g_{m}(1+\eta)} \tag{11.63}
\end{equation*}
$$

### 11.5 SUMMARY

Before summarizing the results of our single-transistor amplifier discussion and proceeding on to more complicated circuits, it is interesting to ask whether we have missed any useful connections. If we concentrate for the sake of discussion on bipolar transistors, there are six possible connections because the input can be applied to any of the three terminals (base, emitter, or collector) and the output can be taken off either one of the other two. The six configurations are presented in Table 11.1.

TABLE 11.1
The six possible single-transistor bipolar amplifier stages.

| Input | Output | Common | Comment |
| :---: | :---: | :---: | :--- |
| E | B | C | Not useful |
| E | C | B | Common-base |
| B | E | C | Emitter-follower |
| B | C | E | Common-emitter and |
|  |  |  | degenerate-emitter |
| C | E | B | Not useful |
| C | B | E | Not useful |

Although all of these connections are possible, as a practical matter taking the output off the base is never useful; nor is applying the input to the collector. This leaves the connections in which (1) the input is applied to the emitter and the output is taken from the collector (common-base), (2) the input is applied to the base and the output is taken from the collector (common-emitter and degenerateemitter), and (3) the input is applied to the base and the output is taken from the emitter (emitter-follower). Notice that for the second case we actually studied two circuits, one in which the third terminal (the emitter in this case) was connected directly to ground (common-emitter) and one in which it went to ground through a feedback resistor (degenerate-emitter). The same choice of adding a resistor between the third terminal and ground exists for the other two cases as well, but neither of the circuits resulting from adding feedback like this are useful. In the common-base arrangement, adding such feedback is a bad idea because the objective in using this circuit is to get a low input resistance; putting a resistor between the base terminal and ground only increases the input resistance. In the emitter-follower arrangement, putting a resistor between the collector and ground does not change any of the mid-band characteristics of the stage and so gains us nothing. Thus we can rest assured that we have identified the complete set of useful single-transistor linear amplifier stages.

The characteristics of these stages are summarized in Table 11.2. Roughly speaking, the common-emitter and common-source stages combine large voltage and current gains, and have moderate-to-large input and output resistances. They have the highest power gain of any of the stages. Adding a resistor to the common terminal to create the degenerate-emitter and degenerate-source stages lowers the gains but at the same time makes them more independent of the device parameters and thus more stable and predictable. The input resistance is also increased.

The common-base and common-gate stages have good voltage gains but their current gains are always less than 1. Their most attractive feature is a low input resistance. The emitter-follower and source-follower stages, on the other hand, are of interest because they have very large input resistances and low output resistances. They have good current gains, but their voltage gains are typically a bit less than 1 .

TABLE 11.2
Summary of the principal characteristics of the useful single-transistor amplifier stages. (Detailed expressions for each of these characteristics for each of the stages can be found in Secs. 11.3 and 11.4 of the text.)

| Stage | $A_{v}$ | $A_{i}$ | $A_{p}$ | $R_{\text {in }}$ | $R_{\text {out }}$ |
| :--- | :--- | :--- | :--- | :--- | :--- |
| Common-emitter <br> Common-source | Large | Large | Large | Medium | Large |
| Degenerate-emitter <br> Degenerate-source | Medium | Medium | Medium | Large | Large |
| Common-base <br> Common-gate | Large | $\leqslant 1$ | Medium | Small | Large |
| Emitter-follower <br> Source-follower | $\leqslant 1$ | Large | Medium | Large | Small |

## PROBLEMS

11.1 Consider the three bipolar transistor bias circuits in Figure 11.2 when $V_{C C}$ is 5 V , $R_{C}$ is $1 \mathrm{k} \Omega, R_{E}$ in Fig. 11.3 c is $2 \mathrm{k} \Omega$, and $R_{B 1}$ in Figs. $11.2 a$ and 11.2 c is 20 $\mathrm{k} \Omega$; assume for this transistor that $V_{B E, O N}=0.6 \mathrm{~V}$ and $\beta_{F}=100$.
(a) Select values for $R_{B 2}$ or $R_{B}$, as appropriate, to result in a quiescent collector current $I_{C}$ of 1 mA .
(b) Imagine that the transistor you used in part a is replaced by one for which $V_{B E, O N}$ is 0.7 V and $\beta_{F}$ is 100 . What is the value of $I_{C}$ in each circuit now, assuming the same resistor values as in part a?
(c) Imagine next that the transistor in part a is replaced by one for which $V_{B E, O N}$ is 0.6 V and $\beta_{F}$ is 75 . Now what is the value of $I_{C}$ in each circuit, assuming the same resistor values as in part a?
(d) Comment on your results in parts b and c. Which bias circuit is more stable (i.e., for which does $I_{C}$ vary the least)?
11.2 (a) What is the open-circuit voltage gain (i.e., $A_{\nu}$ when $R_{L}=\infty$ ) of the circuit in the examples on pages 322 and 333 ?
(b) Redesign the biasing for this circuit so that the input resistance is $10 \mathrm{k} \Omega$. This will require that you change $I_{C}$; keep $V_{C C}$ and $R_{C}$ the same and allow the same output swing (i.e., $\pm 3 \mathrm{~V}$ ).
(c) What is the open-circuit voltage gain of your new circuit?
(d) If $R_{C}$ in this circuit is replaced by a bipolar junction transistor current source, as illustrated in Figure 11.7, and the magnitude of the Early voltage of the npn transistor is 100 V and of the pnp is 50 V , what is the open-circuit voltage gain of the original circuit (i.e., when $I_{C}=1 \mathrm{~mA}$ )? What is the open-circuit voltage gain of the circuit when it is biased as in part b?
11.3 Consider the circuit illustrated in Fig. P11.3. The transistor in this circuit is an $n$-channel enhancement mode MOSFET for which $K$ is $0.1 \mathrm{~mA} / \mathrm{V}^{2}, V_{T}$ is 0.8 V , and $\left|V_{A}\right|$ is 10 V . The two supply voltages, $V_{D D}$ and $V_{S S}$, are +5 V and -5 V , respectively.


FIGURE P11. 3
(a) Select $R_{S}$ and $R_{D}$ so that $I_{D}$ is $0.2 \mathrm{~mA}, V_{\mathrm{IN}}$ is 0 V , and $V_{\text {OUT }}$ is 0 V .
(b) Draw a mid-band linear equivalent circuit for this amplifier valid for operation about the bias point you designed for in part a.
(c) Calculate the mid-band voltage gain $A_{\nu}$ at the bias point in part a for the following load resistor values:
(i) $R_{L}=1 \mathrm{k} \Omega$
(ii) $R_{L}=\infty$
(iii) $R_{L}=10 \mathrm{k} \Omega$
(d) What is the small signal output resistance $R_{\text {out }}$ of this stage for the bias point in part a?
11.4 Consider a common-source amplifier like those in Figure 11.11 but biased using the circuit in Figure 11.3b. Such an amplifier is shown in Fig. P11.4.
(a) Show that $R_{\mathrm{in}}$ is much less than $R_{G}$ and that the reduction can be related to the mid-band voltage gain of this stage.
(b) Derive an expression for the mid-band incremental input resistance $R_{\text {in }}$ of this circuit.
(c) Derive an expression for the incremental output resistance $R_{\text {out }}$ of this circuit.


FIGURE P11.4


FIGURE P11.5
11.5 Consider the four emitter-follower circuits illustrated in Fig. P11.5, all of which have $n$-channel MOSFETs for loads. Notice that two of the circuits ( A and B ) have enhancement mode devices with $V_{T}=1 \mathrm{~V}$ as their loads, and that the other two (C and D ) have depletion mode devices with $V_{T}=-1 \mathrm{~V}$ for loads. $K$ is $0.1 \mathrm{~mA} / \mathrm{V}^{2}$ for both the depletion and enhancement mode devices. $\left|V_{A}\right|$ is 20 V for the MOSFETs and 50 V for the BJTs. Also for the BJTs, $V_{B E, O N}$ is 0.6 V , $V_{C E, S A T}$ is 0.2 V , and $\beta_{F}$ is 100 .
(a) For each of the four circuits, calculate the following parameters:
(i) $V_{\mathrm{IN}, \mathrm{MIN}}$ : the minimum input voltage that will ensure that neither transistor is cut off.
(ii) $V_{\mathrm{OUT}}\left(\nu_{\mathrm{IN}}=V_{\mathrm{IN}, \mathrm{MIN}}\right)$ : the value of $V_{\mathrm{OUT}}$ for $v_{\mathrm{IN}}$ equal to the minimum $\nu_{\text {IN }}$ found in (i).
(iii) VOUT,MAX: the maximum value that the output voltage can have that will still ensure that the circuit will behave as a proper emitter-follower.
(iv) $V_{\text {IN }}\left(v_{\text {OUT }}=V_{\text {OUT, MAX }}\right)$ : the value of $V_{\text {IN }}$ that results in the maximum $v_{\text {OUT }}$ found in (iii).
(v) $I_{C, \mathrm{MAX}}$ : the maximum collector current for $v_{\mathrm{IN}}$ in the range between the values in (i) and (iv).
(vi) $g_{c}\left(v_{\text {OUT }}=V_{C C} / 2\right)$ : the incremental conductance of the MOSFET load transistor when the output voltage is 2.5 V . If the output can never have this value of a particular circuit, state this fact.


FIGURE P11. 6
(b) For circuit D , calculate and sketch the static transfer characteristics, vouT versus $v_{\mathrm{IN}}$, for $0 \leq v_{\mathrm{IN}} \leq 6 \mathrm{~V}$. Indicate the key values of $v_{\mathrm{IN}}$ and $v_{\text {OUT }}$ on the characteristic that separate the various regions. Also indicate the mode of operation of each transistor in each of the regions.
11.6 In the circuit illustrated in Fig. P11.6, $Q_{1}$ is an $n p n$ bipolar transistor with $\beta_{F}=25$ and $v_{B E, O N}=0.6 \mathrm{~V} . Q_{2}$ is an $n$-channel depletion mode MOSFET with $V_{T}=$ -3.5 V , and $K=0.1 \mathrm{~mA} / \mathrm{V}^{2}$.

Notice that the MOSFET is connected so that $v_{G S}$ is zero. Thus its drain current $i_{D}$ is given by $K V_{T}^{2} / 2$, which is about 0.6 mA , for $v_{D S} \geq-V_{T}$ (i.e., for $\left.v_{D S} \geq 3.5 \mathrm{~V}\right)$; and by $K\left(-V_{T}-v_{D S} / 2\right)$, which equals $0.1\left(3.5-v_{D S} / 2\right) v_{D S} \mathrm{~mA}$, for $0 \leq v_{D S} \leq 3.5 \mathrm{~V}$.
(a) (i) For what range of input voltages $v_{\mathrm{IN}}$ between 0 and 4 V will $Q_{1}$ be cut off?
(ii) What is $v_{\text {OUT }}$ in this range?
(b) When $Q_{1}$ just begins to turn on and have nonzero base and collector currents, in what operating region is $Q_{2}$, and why?
(c) (i) What is $v_{\text {OUT }}$ at the boundary between the linear and saturation regions of $Q_{2}$ ?
(ii) What would $v_{\mathrm{IN}}$ have to be to reach this point?
(d) (i) Draw a small-signal linear equivalent circuit for this circuit, valid for operation about the bias point $V_{\text {IN }}=2.6 \mathrm{~V}, V_{\text {OUT }}=2 \mathrm{~V}$. (Note: You should find for this operating point that $Q_{2}$ is biased in its linear region.)
(ii) Calculate the small-signal linear voltage gain $A_{v} \equiv v_{\text {out }} / v_{\text {in }}$ of this circuit for operation about this bias point.
(e) What would happen to $v_{\text {OUT }}$ and to the transistor $Q_{1}$ if $v_{\text {IN }}$ is increased beyond the value you found in (ii) of part c? Discuss briefly.
11.7 For the circuit in Fig. P11.7 we have the following:

$$
\begin{aligned}
& Q_{1}: \beta_{F}=150 ; v_{B E, \mathrm{ON}}=0.6 \mathrm{~V} ; v_{C E, \mathrm{SAT}}=0.2 \mathrm{~V} \\
& Q_{2}: K=1 \mathrm{~mA} / \mathrm{V}^{2} ; V_{T}=1 \mathrm{~V} ; \eta=10^{-2}\left(\text { where } g_{m b}=\eta g_{m}\right) \\
& R_{1}=9 \mathrm{k} \Omega, R_{2}=3 \mathrm{k} \Omega
\end{aligned}
$$



## FIGURE P11.7

$C_{I}, C_{E}$, and $C_{O}$ are all short circuits at the operating frequency.
(a) Select $R_{3}$ so that $I_{C Q}=2 \mathrm{~mA}$.
(b) Calculate the quiescent value of the voltage on the collector of $Q_{1}$ relative to ground.
(c) Draw the mid-band incremental equivalent circuit for this amplifier stage. (Note: $C_{I}, C_{E}$, and $C_{O}$ can be assumed to be short circuits for incremental operation.) Calculate the mid-band incremental voltage gain $A_{\nu} \equiv v_{\text {out }} / v_{\text {in }}$
(d) How far can the output voltage swing positive and negative before either $Q_{1}$ is saturated (negative swing) or $Q_{2}$ is driven out of saturation (positive swing)? Recall that saturation has different meanings in MOSFETs and BJTs.
11.8 In the circuit pictured in Fig. P11.8, $V_{T}$ for both MOSFETs is 0.5 V and the $K$ factor for the lower device, $K_{D}$, is $0.2 \mathrm{~mA} / \mathrm{V}^{2}$. The supply voltage $V_{D D}$ is 5 V . Calculate and plot $\nu_{\text {OUT }}$ versus $\nu_{\text {IN }}$ (i.e., the transfer characteristic) over the range $0 \leq v_{\mathrm{IN}} \leq 5 \mathrm{~V}$ for three values of $K_{L}$ :
(a) $K_{L}=0.01 K_{D}$
(b) $K_{L}=0.1 K_{D}$
(c) $K_{L}=1.0 K_{D}$
(Note: You will find the discussion in Secs. 15.1.4 and 15.2.2a helpful in working this problem.)
11.9 Consider now a situation where the input voltage $\nu_{\text {IN }}$ to the circuit in problem 11.8 is $V_{\mathrm{IN}}+v_{\mathrm{IN}}(t)$, where $V_{\mathrm{IN}}$ is 1 V and $\nu_{\mathrm{in}}(t)$ is "small" and slowly varying with time. We can then in general write $v_{\text {OUT }}$ as $V_{\text {OUT }}+\nu_{\text {out }}(t)$ and in turn write $\nu_{\text {out }}(t)$ as $A_{\nu} v_{\text {in }}(t)$. In this problem we are concerned with finding $V_{\text {OUT }}$ and $A_{\nu}$.
(a) Use your results in problem 11.1 to find a numerical value for $V_{\text {OUT }}$ for each of the three values of $K_{L}$ when $V_{\mathbb{N N}}$ is $1 \mathrm{~V} . A_{y}$ can be found in several ways. Follow the two procedures described below in parts b and c to find $A_{v}$ when $K_{L}$ has each of the three values given in problem 11.8.
(b) $A_{v}$ is $d v_{\text {OUT }} / d v_{\text {IN }}$ evaluated at the bias point $\ddot{Q}$ (i.e., $V_{\mathrm{IN}}=\overline{1} \overline{\mathrm{~V}}$ ). Use your expressions or plots from problem 11.1 to find $A_{\nu}$ from this fact.
(c) $A_{v}$ is $v_{\text {out }} / v_{\text {in }}$ in the circuit formed by replacing the devices in this circuit with their small-signal linear equivalent circuits valid for this bias point as illustrated


## FIGURE P11.8

in Fig. P11.9a, which you should be able to convince yourself is equivalent to Fig. P11.9b.
(i) Evaluate $g_{m D}$ and $g_{m L}$ at this bias point for each of the circuits (i.e., for each $K_{L}$ value).
(ii) Calculate $v_{\text {out }} / \nu_{\text {in }}$ for each of the circuits, and compare your answers with those from part a. Assume that $g_{o D}$ and $g_{o L}$ are zero in saturation.
11.10 A measure of the maximum voltage gain achievable with a given transistor is its mid-band linear incremental voltage gain in a common-emitter or common-source configuration with an infinite load resistance (i.e., when it is incrementally opencircuited). We call this, not surprisingly, the mid-band open-circuit voltage .gain $A_{\text {voc }}$.
(a) Show that $A_{\text {voc }}$ is $-g_{m} / g_{o}$ for both BJTs and MOSFETs (assume $v_{b s}=0$ ).
(b) Use our expressions for $g_{m}$ and $g_{o}$ in the forward active region in terms of the quiescent output current ( $I_{C}$ or $I_{D}$ ) and other device parameters to find an expression for $A_{\text {voc }}$ in terms of these same quantities. Do this for a BJT and for a MOSFET.


FIGURE P11.9a


FIGURE P11.9b
(c) Calculate $A_{\text {voc }}$ for a BJT assuming $V_{A}=50 \mathrm{~V}, I_{C}=0.1 \mathrm{~mA}, \beta=100$, and $k T / q=0.025 \mathrm{~V}$.
(d) Calculate $A_{\text {voc }}$ for a MOSFET assuming $V_{A}=50 \mathrm{~V}, I_{D}=0.1 \mathrm{~mA}, K=0.2$ $\mathrm{mA} / \mathrm{V}^{2}$, and $V_{T}=0.5 \mathrm{~V}$.
(e) In parts c and d , how will $A_{\mathrm{voc}}$ change if the quiescent output current, $I_{C}$ or $I_{D}$, is decreased?
11.11 Use the basic large-signal MOSFET model to derive expressions for the terminal characteristics of each of the four MOSFET loads illustrated in Figure 11.12. Show that your results yield the curves presented in that figure.
11.12 Consider the amplifier circuit illustrated in Fig. P11.12.
(a) Assuming $R_{G}$ can be made arbitrarily large and can be neglected, derive an expression for the small-signal open-circuit voltage gain of this amplifier ( $A_{v, 00}$ $\equiv v_{\text {out }} / v_{\text {in }}$ with no external load). State your result in terms of the quiescent collector/drain current and the Early voltages of $Q_{1}$ and $Q_{2}$. Suggest the optimum bias level.
(b) Now assume that $R_{G}$ can no longer be made so large that it can be neglected. Derive an expression for $A_{v, \text { oc }}$ in this case and compare it to your result in part a.


FIGURE P11.12
(c) Develop a design rule an engineer could use to "size" $R_{G}$ in a given situation so that its impact on $A_{\nu, o c}$ is negligible.
(d) Design a circuit like this (i.e., an enhancement mode MOSFET amplifier with a $p n p$ bipolar transistor load) that does not use $R_{G}$ to bias the MOSFET $Q_{1}$. (Hint: One possibility is to use the approach taken in the circuits in Figs. 11.7 and 11.16.)

## CHAPTER

 12
## DIFFERENTIAL AMPLIFIER STAGES

Thus far the amplifier circuits we have studied have had one input and one output. We now turn to a fundamentally different amplifier topology that has two inputs and two outputs. The outputs are related primarily to the difference between the two inputs, and consequently we call this type of amplifier a difference, or differential, amplifier. Because of its topology, it is also called an emitter-coupled pair when bipolar transistors are used as the active devices, or a source-coupled pair when FETs are used.

We will begin by looking at the basic differential amplifier stage. We will next consider the large-signal behavior of this circuit and then discuss its smallsignal linear analysis. Finally, in Sec. 12.4, we will discuss the design of the current source circuits used to bias these amplifiers.

### 12.1 BASIC TOPOLOGY

The basic differential amplifier topology is illustrated in Fig. 12.1; the circuit in Fig. $12.1 a$ is made with bipolar transistors, and the circuit of Fig. $12.1 b$ uses MOSFETs. The qualitative behavior of both of these circuits is the same. The differential amplifier circuit is a perfectly symmetrical topology; both transistors are identical, as are each of the resistor pairs. Biasing is accomplished using a current source, and, because of the symmetry, half of the bias current flows through each transistor.

The operation of the circuits in Fig. 12.1 can be understood by first considering what happens when the two input voltages, $v_{I 1}$ and $v_{I 2}$, are identical. Because of the symmetry of the circuit, there will clearly be no change in the current through the two transistors, $Q$, or through the output resistors, $R_{O}$, as


FIGURE 12.1
Basic differential amplifier topology: (a) circuit made using bipolar transistors as the active elements, also called an emitter-coupled pair; (b) the MOSFET version of the same circuit, also called a source-coupled pair.
$v_{I 1}$ and $v_{I 2}$ vary, as long as $v_{I 1}=v_{I 2}$. Thus there will also be no change in either of the two output voltages. They will stay fixed at $V_{C C}-R_{O} I_{\text {BIAS }} / 2$ in the bipolar circuit and $V_{D D}-R_{O} I_{\mathrm{BLAS}} / 2$ in the MOSFET circuit.

If the two inputs are different, then the symmetry of the circuit is broken and the current $I_{\text {BIAs }}$ no longer splits evenly between the two halves of the circuit. One of the output voltages will increase, and the other will decrease.


FIGURE 12.2
Two variations of the basic differential amplifier: (a) differential stage with emitter degeneracy; (b) differential source-follower.

Often we will take the difference between the two output voltages $v_{O 1}$ and $v_{O 2}$ as the output $v_{O}$. Clearly this difference will be zero if $v_{T 1}=v_{T 2}$ and nonzero only if $v_{T 1} \neq v_{T 2}$.

There are many variations of the basic differential amplifier. All are symmetrical, however, and all use current source biasing; most correspond to one of the various single-transistor stage configurations discussed in Chap. 11. For example, the circuits of Figs. $12.1 a$ and $b$ correspond to a common-emitter stage and a common-source stage, respectively. Differential amplifier stages analogous to a single-transistor stage with emitter degeneracy and a source-follower stage are shown in Figs. $12.2 a$ and $b$, respectively. We will focus our analyses on the circuit of Figs. 12.1, but it should become clear to you as we go along that these analyses can readily be extended to other configurations, such as those of Fig. 12.2.

### 12.2 LARGE-SIGNAL ANALYSIS

To quantify our understanding of differential amplifier stages we will first consider a large-signal analysis of the bipolar stage of Fig. $12.1 a$ using the Ebers-Moll model, and then we will do the same exercise for the MOSFET differential amplifier of Fig. 12.1b. In both cases, we will begin by considering a general pair of inputs that can have any values as long as the transistors $Q_{1}$ and $Q_{2}$ remain in their forward active region. After calculating the transfer characteristics (i.e., the output voltages as a function of the input voltages) for a general set of inputs, we will look at a way of defining a new set of inputs with important symmetry properties that will simplify the analysis of differential amplifier stages. We will call these the difference and common mode inputs.

### 12.2.1 Bipolar Differential Amplifier Transfer Characteristic

In Fig. 12.3, the transistors $Q_{1}$ and $Q_{2}$ in the amplifier of Fig. 12.1 have been replaced by their Ebers-Moll model equivalent circuits from Fig. 8.18. Our objective now is to calculate $v_{O 1}$ and $v_{O 2}$ and, later, $v_{O}$, which is $v_{O 1}-v_{O 2}$, each as a function of $v_{I 1}$ and $v_{I 2}$. The relationship between $v_{O}$ and $v_{I}$ for a circuit is called its transfer characteristic.

Begin by writing the output voltages in terms of $i_{F 1}$ and $i_{F 2}$ :

$$
\begin{align*}
v_{O 1} & =V_{C C}-R_{C} \alpha_{F} i_{F 1}  \tag{12.1a}\\
v_{O .2} & =V_{C C}-R_{C} \alpha_{F} i_{F 2}  \tag{12.1b}\\
v_{O} & =-R_{C} \alpha_{F}\left(i_{F 1}-i_{F 2}\right) \tag{12.1c}
\end{align*}
$$

The currents $i_{F 1}$ and $i_{F 2}$ can now be written in terms of $v_{B E 1}$ and $v_{B E 2}$ :

$$
\begin{align*}
& i_{F 1} \approx I_{E S} e^{q \nu_{B E 1} / k T}  \tag{12.2a}\\
& i_{F 2} \approx I_{E S} e^{q \nu_{B E 2} / k T} \tag{12.2b}
\end{align*}
$$

where we have assumed that $v_{B E} \gg k T / q$, so the factor of 1 can be neglected. Using these expressions in Eqs. (12.1a) and (12.1b) yields


FIGURE 12.3
Differential amplifier of Fig. $12.1 a$ with Ebers-Moll models for the npn bipolar transistors.

$$
\begin{align*}
& v_{O 1}=V_{C C}-R_{C} \alpha_{F} I_{E S} e^{q v_{B E 1} / k T}  \tag{12.3a}\\
& v_{O 2}=V_{C C}-R_{C} \alpha_{F} I_{E S} e^{q v_{B E 2} / k T} \tag{12.3b}
\end{align*}
$$

The next step is to sum the currents out of the common emitter node:

$$
\begin{equation*}
i_{F 1}+i_{F 2}=I_{\mathrm{BIAS}} \tag{12.4}
\end{equation*}
$$

Using Eqs. (12.2) in this yields

$$
\begin{equation*}
I_{\mathrm{BIAS}}=I_{E S}\left(e^{q v_{B E 1} / k T}+e^{q v_{B E 2} / k T}\right) \tag{12.5}
\end{equation*}
$$

This equation can be used to obtain expressions for $v_{O 1}$ and $v_{O 2}$ in terms of $v_{B E 1}-v_{B E 2}$. This is important because by summing the voltages around the loop through the two emitters and ground, we can also write

$$
v_{I 1}-v_{B E 1}+v_{B E 2}-v_{I 2}=0
$$

or

$$
\begin{equation*}
v_{B E 1}-v_{B E 2}=v_{I 1}-v_{I 2} \tag{12.6}
\end{equation*}
$$

This in turn lets us relate $v_{O 1}$ and $v_{O 2}$ to $v_{I 1}$ and $v_{I 2}$, which is our goal.
Proceeding, we focus first on $v_{B E 1}$ and $v_{O 1}$. A bit of algebraic manipulation of Eq. (12.5) yields

$$
e^{q \nu_{B E 1} / k T}=\frac{I_{\mathrm{BIAS}}}{I_{E S}\left[1+e^{-q\left(v_{B E 1}-v_{B E 2}\right) / k T}\right]}
$$

Inserting this into Eq. (12.3a) and using Eq. (12.6), we obtain

$$
\begin{equation*}
v_{O 1}=V_{C C}-\frac{\alpha_{F} R_{C} I_{\mathrm{BIAS}}}{\left[1+e^{-q\left(v_{I 1}-v_{I 2}\right) / k T}\right]} \tag{12.7a}
\end{equation*}
$$

A similar examination of Eq. (12.3b) yields

$$
\begin{equation*}
v_{O 2}=V_{C C}-\frac{\alpha_{F} R_{C} I_{\mathrm{BIAS}}}{\left[1+e^{q\left(v_{11}-v_{I 2}\right) / k T}\right]} \tag{12.7~b}
\end{equation*}
$$

Finally, subtracting Eq. (12.7a) from Eq. (12.7b), we find, after a bit more algebraic manipulation, that $v_{O}$ can be written as

$$
\begin{equation*}
v_{O}=-\alpha_{F} R_{C} I_{\mathrm{BIAS}} \tanh \frac{q\left(v_{I 1}-v_{I 2}\right)}{2 k T} \tag{12.7c}
\end{equation*}
$$

The important thing to notice about Eqs. (12.7) for the various output voltages is that all of these output voltages depend only on the difference between the input voltages. If $v_{I 1}$ is equal to $v_{I 2}$, then $v_{O 1}$ and $v_{O 2}$ equal their quiescent values, $V_{C C}-R_{C} I_{\mathrm{BIAS}} / 2$, and $v_{O}$ is zero. Change in the output occurs only if $v_{I 1}$ is not equal to $v_{I 2}$, just as we argued qualitatively in Sec. 12.1.

It is instructive to plot Eq. (12.7c), the expression for $v_{O}$, as a function of $\left(v_{I 1}-v_{I 2}\right)$, as is done in Fig. 12.4. The first thing to notice is that for $\left|\left(v_{I 1}-v_{I 2}\right)\right| \gg k T / q$, the output voltage saturates at $\pm \alpha_{F} R_{C} I_{\text {BIAS }}$, which says


FIGURE 12.4
The large signal transfer characteristic of the circuit in Fig. 12.1a calculated using the model of Fig. 12.3.
that all of the current source current has been switched to flow totally through $Q_{1}$ when $\left(v_{I 1}-v_{I 2}\right) \gg 0$, or through $Q_{2}$. when $\left(v_{I 1}-v_{I 2}\right) \ll 0$.

For $\left|\left(v_{I 1}-v_{I 2}\right)\right|$ small, on the other hand, $v_{O}$ varies linearly with $\left(v_{I 1}-v_{I 2}\right)$, that is,

$$
\begin{equation*}
v_{O}=\frac{-R_{C} q \alpha_{F} I_{\mathrm{BIAS}}}{2 k T}\left(v_{I 1}-v_{I 2}\right) \tag{12.8a}
\end{equation*}
$$

for $\left|\left(v_{I 1}-v_{I 2}\right)\right| \leqslant k T / q$.
Notice that $q \alpha_{F} I_{\mathrm{BIAS}} / 2 k T$ is the small-signal transconductance $g_{m}$. of the transistors $Q_{1}$ and $Q_{2}$ for operation about the quiescent bias point $I_{C}=$ $\alpha_{F} I_{\text {BIAS }} / 2$. Thus Eq. (12.8a) can also be written as

$$
\begin{equation*}
v_{O} \approx-g_{m} R_{C}\left(v_{I 1}-v_{I 2}\right) \tag{12.8b}
\end{equation*}
$$

for $\left|\left(v_{I 1}-v_{I 2}\right)\right| \leq k T / q$. We will return to this point when we look at small-signal analysis of differential amplifiers.

### 12.2.2 MOSFET Differential Amplifier Transfer Characteristic

To calculate the transfer characteristic of the common-source MOSFET differential amplifier stage in Fig.12.1b, we use our large-signal model of Sec.10.1.1 to obtain the circuit of Fig. 12.5. Looking at this circuit we see, first, that the output voltage $v_{O}$ is given by

$$
v_{O}=-R_{D}\left(i_{D 1}-i_{D 2}\right)
$$

Assuming that both $Q_{1}$ and $Q_{2}$ are operating in saturation, we have

$$
\begin{align*}
i_{D 1} & =\frac{K}{2}\left(v_{G S 1}-V_{T}\right)^{2}  \tag{12.9a}\\
i_{D 2} & =\frac{K}{2}\left(v_{G S 2}-V_{T}\right)^{2} \tag{12.9b}
\end{align*}
$$



FIGURE 12.5
Differential amplifier of Fig. $12.1 b$ with large-signal model of Sec. 10.1.1 inserted for the $n$-channel enhancement mode MOSFETs.
so we can write

$$
\begin{equation*}
v_{O}=-\frac{R_{D} K}{2}\left[\left(v_{G S 1}-V_{T}\right)^{2}-\left(v_{G S 2}-V_{T}\right)^{2}\right] \tag{12.10}
\end{equation*}
$$

Before going further it is important to understand why we can assume that both $Q_{1}$ and $Q_{2}$ have the same threshold voltage $V_{T}$ in light of the fact that $V_{T}$ depends on $v_{B S}$. In an integrated circuit, which is the context in which this circuit would be realized, both transistors share a common substrate, and their sources are already joined in the circuit, so clearly $v_{B S}$ is the same for these two transistors. Thus we do not need to write $V_{T 1}$ and $V_{T 2}$; there is only one $V_{T}$.

Returning to Eq.(12.10), we observe that it is of the form

$$
\begin{equation*}
v_{O}=-\frac{R_{D} K}{2}\left(a^{2}-b^{2}\right) \tag{12.11a}
\end{equation*}
$$

where $a$ is $\left(v_{G S 1}-V_{T}\right)$ and $b$ is $\left(v_{G S 2}-V_{T}\right)$. We can next write $v_{O}$ in Eq. 12.11a as

$$
\begin{equation*}
v_{O}=-\frac{R_{D} K}{2}(a-b)(a+b) \tag{12.11b}
\end{equation*}
$$

This is useful because the first factor, $(a-b)$, is related to the input voltages, $v_{I 1}$ and $v_{I 2}$. To see this we first write

$$
\begin{equation*}
(a-b)=v_{G S 1}-V_{T}-v_{G S 2}+V_{T}=v_{G S 1}-v_{G S 2} \tag{12.12a}
\end{equation*}
$$

Then, using Kirchhoff's voltage law and summing around the path that includes the two inputs and passes through the common source terminals, we have

$$
\begin{equation*}
-v_{I 1}+v_{G S 1}-v_{G S 2}+v_{I 2}=0 \tag{12.12b}
\end{equation*}
$$

Thus,

$$
\begin{equation*}
v_{G S 1}-v_{G S 2}=v_{I 1}-v_{I 2} \tag{12.12c}
\end{equation*}
$$

and so we have

$$
\begin{equation*}
(a-b)=\left(v_{I 1}-v_{I 2}\right) \tag{12.12d}
\end{equation*}
$$

The other factor, $(a+b)$, can be written as

$$
\begin{equation*}
(a+b)=\sqrt{2\left(a^{2}+b^{2}\right)-(a-b)^{2}} \tag{12.13a}
\end{equation*}
$$

(an obscure identity, but true). We already know ( $a-b$ ); an expression for ( $a^{2}+b^{2}$ ) can be obtained by using the restriction that $i_{D 1}$ and $i_{D 2}$ must sum to $I_{\mathrm{BIAS}}$. That is,

$$
\begin{equation*}
I_{\mathrm{BIAS}}=\frac{K}{2}\left[\left(v_{G S 1}-V_{T}\right)^{2}+\left(v_{G S 2}-V_{T}\right)^{2}\right] \tag{12.14a}
\end{equation*}
$$

which, using our notation, has the form

$$
\begin{equation*}
I_{\mathrm{BIAS}}=\frac{K}{2}\left(a^{2}+b^{2}\right) \tag{12.14b}
\end{equation*}
$$

So

$$
\begin{equation*}
\left(a^{2}+b^{2}\right)=\frac{2 I_{\mathrm{BIAS}}}{K} \tag{12.14c}
\end{equation*}
$$

and thus

$$
\begin{equation*}
(a+b)=\sqrt{\frac{4 I_{\mathrm{BIAS}}}{K}+\left(v_{I 1}-v_{I 2}\right)^{2}} \tag{12.13b}
\end{equation*}
$$

Combining Eq. (12.12d) and (12.13b) in Eq. (12.11b) yields our final result:

$$
\begin{equation*}
v_{O}=-\frac{R_{D} K}{2}\left(v_{I 1}-v_{I 2}\right) \sqrt{\frac{4 I_{\mathrm{BIAS}}}{K}-\left(v_{I 1}-v_{I 2}\right)^{2}} \tag{12.15}
\end{equation*}
$$

We first note that $v_{O}$ again depends only on the difference between the two input voltages, as we argued must be the case in Sec. 12.1. This large-signal transfer characteristic is plotted in Fig. 12.6. For $v_{I 1}$ much larger than $v_{I 2}, v_{O}$ saturates at $-R_{D} I_{\text {BIAS }}$, which corresponds to having all the bias current flow through $Q_{1}$


FIGURE 12.6
Large-signal transfer characteristic of the circuit in Fig. 12.1b as modeled in Fig. 12.5.
and none through $Q_{2}$. In the opposite extreme, when $\nu_{I 2}$ is much greater than $v_{I 1}, v_{O}$ saturates at $R_{D} I_{\text {BIAS }}$ because $I_{\text {BIAS }}$ now flows entirely through $Q_{2}$.

For $v_{I N 1}$ similar to $v_{I N 2}$ so that $\left|\left(v_{I 1}-v_{I 2}\right)\right|$ is small, $v_{O}$ depends approximately linearly on this difference. That is,

$$
\begin{equation*}
v_{O} \approx-R_{D} \sqrt{I_{\mathrm{BIAS}} K}\left(v_{I 1}-v_{I 2}\right) \tag{12.16a}
\end{equation*}
$$

when $\left|\left(v_{I 1}-v_{I 2}\right)\right| \ll\left(I_{\mathrm{BIAS}} / K\right)^{1 / 2}$. Noting next that the drain current is $I_{\mathrm{BIAS}} / 2$ when the two input voltages are equal, and recalling Eq. 10.2 b relating $g_{m}$ to $I_{D Q}$, we see that $\left(I_{\mathrm{BIAS}} K\right)^{1 / 2}$ is the small-signal transconductance of $Q_{1}$ and $Q_{2}$ at this bias point; thus we have

$$
\begin{equation*}
v_{O} \approx-g_{m} R_{D}\left(v_{I 1}-v_{I 2}\right) \tag{12.16b}
\end{equation*}
$$

which is identical to the bipolar result, Eq. (12.8).
The transfer characteristic in Fig. 12.6 will have to be modified if the transistors go out of saturation and into their linear regions for $\left|\left(v_{I 1}-v_{I 2}\right)\right|$ less than $\left(2 I_{\mathrm{BIAS}} / K\right)^{1 / 2}$. However, the transfer characteristic will still be symmetrical, will depend only on $\left(v_{I 1}-v_{I 2}\right)$, and will have the same slope at the origin and the same maximum values for $\left|\left(v_{I 1}-v_{I 2}\right)\right|$ large.

### 12.2.3 Difference and Common Mode Inputs

We have just seen, first qualitatively and then quantitatively, that the output voltage of a differential amplifier depends only on the difference between the two inputs. This observation leads us to define difference mode input and common mode input voltages, $v_{I D}$ and $v_{I C}$, respectively, as

$$
\begin{gather*}
v_{I D} \equiv v_{I 1}-v_{I 2}  \tag{12.17a}\\
v_{I C} \equiv \frac{\left(v_{I 1}+v_{I 2}\right)}{2} \tag{12.17b}
\end{gather*}
$$

We note that any arbitrary set of two inputs, $v_{I 1}$ and $v_{I 2}$, can be written in terms of the difference mode input $v_{I D}$ and the common mode input $v_{I C}$ as follows:

$$
\begin{align*}
& v_{I 1}=v_{I C}+\frac{v_{I D}}{2}  \tag{12.18a}\\
& v_{I 2}=v_{I C}-\frac{v_{I D}}{2} \tag{12.18b}
\end{align*}
$$

Looking at the inputs in this manner, we can say that the output of a differential amplifier is independent of the common mode input signal $v_{I C}$. It depends only on the difference mode input signal $v_{I D}$.

The transfer characteristics, Eqs. (12.7) and (12.15) and Figs. 12.4 and 12.6, teach us that the magnitude of the difference mode input signal $v_{I D}$ must be less than $2 k T / q$ for a bipolar differential amplifier and less than $\left(I_{\text {BIAS }} / K\right)^{1 / 2}$ for a MOSFET differential amplifier, or the output voltage will saturate and become independent of $v_{I D}$. This usually is not a very useful situation, so we tend to operate with small $v_{I D}$.

There is also a restriction on how large the magnitude of the common voltage signal $v_{I C}$ can be, but it is not found by looking at the transfer characteristic. Rather it arises because of the requirement that the transistors remain in their forward active regions. Looking at the bipolar circuit, Fig. $12.1 a$ for example, we see that if the two input terminals become too positively biased, the transistors will saturate because their collector voltages are fixed at $V_{C C}-R_{C} I_{\mathrm{BIAS}} / 2$ relative to ground. Clearly we must have $v_{I C}<V_{C C}-R_{C} I_{\text {BIAS }} / 2+0.4 \mathrm{~V}$, assuming $v_{C E, S A T} \approx 0.2 \mathrm{~V}$ and $v_{B E, \mathrm{ON}} \approx 0.6 \mathrm{~V}$. When the two input terminals are biased negatively, the limit on $v_{I C}$ arises from the transistors making up the bias current source (i.e., providing $I_{\text {BIAS }}$ ). For $v_{I C}$ sufficiently negative, one of these transistors will saturate (which one will be obvious when we discuss current source circuits in Sec. 12.5) and the current source circuit will no longer be operating properly.

The permissible range of common mode voltages is called the common mode voltage swing and is one of the performance parameters often quoted for a differential amplifier stage.

### 12.3 SMALL-SIGNAL LINEAR ANALYSIS

We will make great use of the concept of difference and common mode input signals in our small-signal analysis of differential amplifiers. The symmetry of these inputs and the symmetry and linearity of the circuit can be combined to yield very powerful analytical techniques. We will first discuss these techniques, called half-circuit techniques, in rather general, abstract terms. We will then apply them to calculate the small-signal linear gains and the input and output resistances of differential amplifiers.

### 12.3.1 Half-Circuit Techniques

Consider a symmetrical circuit with two input terminals and two output terminals like that shown in Fig. 12.7a. This circuit can be divided into two identical halfcircuits connected by a number of links as shown in Fig.12.7b.

If the same voltage $v_{I C}$ is applied to the two inputs, as illustrated in Fig. 12.8 , we can see right away by symmetry that the voltages on the two output terminals must be equal; that is,

$$
\begin{equation*}
v_{O 1}=v_{O 2} \equiv v_{O C} \quad \text { when } \quad v_{I 1}=v_{I 2}=v_{I C} \tag{12.19}
\end{equation*}
$$

Furthermore, we can say on the basis of symmetry that there must be no current flowing in any of the links that join the two halves of the circuit. The argument is that because of the total symmetry in the circuit, there is no reason a current in any of the links should flow one way rather than the other. The only consistent condition is that the current is zero.

If there is no current flowing in any of the links, then they can be cut without affecting the circuit. Thus we can determine what $v_{O C}$ will be, given $v_{I C}$, simply by breaking all of the links and solving half of the circuit. This is illustrated in


FIGURE 12.7
(a) Symmetrical circuit; (b) two identical half-circuits connected by a number of conducting links.

Fig.12.8. This observation has practical significance because the newly created half-circuit for common mode inputs will in general be much simpler to solve than the original full circuit.

If equal but opposite voltages $v_{I D}$ and $-v_{I D}$ are applied to the inputs $v_{I 1}$ and $v_{I 2}$, respectively, we can in general realize a similar simplification of a symmetrical circuit only in the special situation where the circuit is linear and contains no independent sources. This sounds a bit restrictive until you realize that this is just the type of circuit we encounter when we do our small-signal analyses.

Consider, then, a symmetrical linear small-signal equivalent circuit with two inputs, two outputs, and no independent sources. With equal, but opposite voltages $v_{i d}$ and $-v_{i d}$ applied to the inputs $v_{i 1}$ and $v_{i 2}$, respectively, the outputs must, by symmetry, also be equal and opposite; that is,

$$
\begin{equation*}
v_{o 1}=-v_{o 2} \equiv v_{o d} \quad \text { when } \quad v_{i 1}=-v_{i 2}=v_{i d} \tag{12.20}
\end{equation*}
$$

To see mathematically why this must be true, realize that since the circuit is linear and has no independent sources, we must be able to write $v_{o 1}$ and $v_{o 2}$ as follows:


FIGURE 12.8
(a) Symmetrical circuit with common mode input signals applied;
(b) half-circuit equivalent.

$$
\begin{align*}
& v_{o 1}=A v_{i 1}+B v_{i 2}  \tag{12.21a}\\
& v_{o 2}=A v_{i 2}+B v_{i 1} \tag{12.21b}
\end{align*}
$$

Requiring the circuit to be linear means that the highest-order terms can at most be linear terms; requiring no independent sources means that there will be no constant term; and requiring the circuit to be symmetrical means that these expressions are symmetrical. Now, if $v_{i 1}=-v_{i 2}=v_{i d}$, we have directly from Eqs. (12.21a) and (12.21b) that $v_{o 1}=-v_{o 2}=v_{o d}$.

We can also say something about the voltage differences between any of the links between the two half-circuits. In particular, they must be zero, since they are zero in the absence of any input voltages and there is no reason they should increase or decrease when an input voltage to the right is increased a certain amount and that on the left is decreased by the same amount. The only consistent situation is that they remain at 0 V .

Mathematically, it must be true that the voltage, measured relative to some reference point (say, ground), at any point of symmetry in a symmetrical circuit
depends in an identical way on both of the input signals. That is, if the point of symmetry in question is labeled "a", then we must have

$$
\begin{equation*}
v_{a}=C v_{i 1}+C v_{i 2} \tag{12.22a}
\end{equation*}
$$

or simply

$$
\begin{equation*}
v_{a}=C\left(v_{i 1}+v_{i 2}\right) \tag{12.22b}
\end{equation*}
$$

Thus, if $v_{i 1}=-v_{i 2}$, then clearly $v_{a}=0$.
This result is the difference mode input equivalent to saying that the current in the links is zero with a common mode input. It has similar implications for the circuit. In particular, if all of the links stay at 0 V (i.e., ground potential) when $v_{i 1}=-v_{i 2}$, then they can all be connected together and grounded without affecting the circuit operation. Thus we can obtain $v_{o d}$ in terms of $v_{i d}$ by shorting all of the links to ground and solving for the voltages in one of the resulting half-circuits. This procedure is illustrated in Fig. 12.9. It is not hard to imagine that shorting all of the links together can simplify the analysis of the remaining new half-circuit immensely.


FIGURE 12.9
(a) Symmetrical linear circuit with difference mode input signals applied;
(b) Half-circuit equivalent.

These half-circuit observations are useful in several ways when we are analyzing differential amplifiers, which tend to be very symmetrical circuits. The first instance is for bias analysis. From a bias standpoint, the inputs are zero, which certainly means they are equal, or common mode, and this means that we can use our common mode half-circuit techniques to calculate the quiescent currents and voltages in the circuit. This is sometimes useful, and we already made use of it when we said that half of the bias current flows through each half of a differential pair.

The second application of half-circuit techniques in differential amplifier design is for small-signal linear equivalent circuit analysis. Here the impact of half-circuit techniques is much more significant because we can now also make use of superposition. That is, in general, two arbitrary inputs, $v_{I 1}$ and $v_{I 2}$, can be written in terms of a common and a difference mode input, as we saw in Sec. 12.2.3. If we are dealing with linear circuits, we can find the output signals due to each of these inputs (i.e., the common and difference mode inputs) individually and we can use superposition to reconstruct the total response.

To do this type of analysis, we first define small-signal difference and common mode signals in terms of $v_{i 1}$ and $v_{i 2}$ :

$$
\begin{align*}
& v_{i c} \equiv \frac{\left(v_{i 1}+v_{i 2}\right)}{2}  \tag{12.23a}\\
& v_{i d} \equiv v_{i 1}-v_{i 2} \tag{12.23b}
\end{align*}
$$

Writing the inputs in terms of these quantities, we have simply

$$
\begin{align*}
& v_{i 1}=v_{i c}+\frac{v_{i d}}{2}  \tag{12.24a}\\
& v_{i 2}=v_{i c}-\frac{v_{i d}}{2} \tag{12.24b}
\end{align*}
$$

Thus we can first use half-circuit techniques to solve for the output voltages with $v_{i 1}=v_{i c}$ and $v_{i 2}=v_{i c}$. In this case, as we have said, we find $v_{o 1}=v_{o 2} \equiv v_{o c}$. Then we use half-circuit techniques to solve for the output voltages with $v_{i 1}=v_{i d}$ and $v_{i 2}=-v_{i d}$. In this case we obtain $v_{o 1}=-v_{o 2} \equiv v_{o d}$. Having $v_{o d}$ and $v_{o c}$ we superimpose these results to obtain the total output voltages

$$
\begin{align*}
& v_{o 1}=v_{o c}+\frac{v_{o d}}{2}  \tag{12.25a}\\
& v_{o 2}=v_{o c}-\frac{v_{o d}}{2} \tag{12.25b}
\end{align*}
$$

The advantage of this approach is that it is in general much easier to find $v_{o d}$ and $v_{o c}$ given $v_{i d}$ and $v_{i c}$ using half-circuit techniques than it is to calculate $v_{o 1}$ and $v_{o 2}$ given $v_{i 1}$ and $v_{i 2}$ using the entire circuit and without taking advantage of the symmetry of the problem. All of these points are best understood with a few examples, which we will turn to next.

### 12.3.2 Difference and Common Mode Voltage Gains

We know already that a differential amplifier responds differently to a difference mode input signal than it does to a common mode input signal. To quantify this difference we define two voltage gains, the difference mode voltage gain $A_{v d}$ and the common mode voltage gain $A_{\nu c}$ as follows:

$$
\begin{align*}
A_{\nu d} & \equiv \frac{v_{o d}}{v_{i d}}  \tag{12.26}\\
A_{\nu c} & \equiv \frac{v_{o c}}{v_{i c}} \tag{12.27}
\end{align*}
$$

If we know $A_{\nu d}$ and $A_{\nu c}$ for a circuit, its output voltages can be found for a given set of input voltages. Consider, for example, $v_{o 1}$ :

$$
\begin{equation*}
v_{o 1}=v_{o c}+\frac{v_{o d}}{2} \tag{12.28a}
\end{equation*}
$$

From Eqs. (12.26) and (12.27) this becomes

$$
\begin{equation*}
v_{o 1}=A_{v c} v_{i c}+A_{v d} \frac{v_{i d}}{2} \tag{12.28b}
\end{equation*}
$$

Then, using the definitions of $v_{i c}$ and $v_{i d}$, we find

$$
\begin{equation*}
v_{o 1}=A_{v c} \frac{\left(v_{i 1}+v_{i 2}\right)}{2}+A_{v d} \frac{\left(v_{i 1}-v_{i 2}\right)}{2} \tag{12.28c}
\end{equation*}
$$

or, rearranging,

$$
\begin{equation*}
v_{o 1}=\left[\frac{\left(A_{\nu c}+A_{\nu d}\right)}{2}\right] v_{i 1}+\left[\frac{\left(A_{v c}-A_{\nu d}\right)}{2}\right] v_{i 2} \tag{12.28d}
\end{equation*}
$$

Similarly we can find

$$
\begin{equation*}
v_{o 2}=\left[\frac{\left(A_{\nu c}-A_{\nu d}\right)}{2}\right] v_{i 1}+\left[\frac{\left(A_{\nu c}+A_{\nu d}\right)}{2}\right] v_{i 2} \tag{12.29}
\end{equation*}
$$

and finally

$$
\begin{equation*}
v_{o}=A_{v d}\left(v_{i 1}-v_{i 2}\right) \tag{12.30}
\end{equation*}
$$

The careful reader will notice that we said earlier in our large-signal analyses that the output voltages do not depend on the common mode input signal [see Eqs.(12.7, for example)], yet Eq. (12.28b) involves $v_{i c}$. Thus unless $A_{\nu c}$ is zero, the output voltages $v_{o 1}$ and $v_{o 2}$ do depend on $v_{i c}$. What is going on, as we shall quantify very shortly, is that our discussion in Sec. 12.2 assumed that the bias current is supplied by an ideal current source. If the current source is indeed ideal, then we will find that $A_{\nu c}$ is identically zero, as is consistent with our earlier discussion. If, however, the current source is not ideal, but instead has a finite output resistance, then $A_{\nu c}$ will be nonzero (albeit very, very small) and $v_{o 1}$ and $v_{o 2}$ will depend very slightly on $v_{i c}$. Notice, however, that $v_{o}$, which equals ( $v_{o 1}-v_{o 2}$ ), never depends on $v_{o c}$, even if the current source is not ideal.

The above discussion can be quantified by introducing what is called the common mode rejection ratio (CMRR). CMRR is defined as the ratio of the output voltage $v_{o 1}$ that results from a difference mode input signal $v_{i d}$ to the output voltage that results from an identical common mode input signal $v_{i c}$. We have

$$
\begin{equation*}
\mathrm{CMRR} \equiv \frac{A_{\nu d}}{A_{\nu c}} \tag{12.31}
\end{equation*}
$$

The idea is to make this quantity as large as possible.
Now we look at calculating $A_{\nu c}$ and $A_{v d}$ for some specific circuits as a way of illustrating the preceding discussions. As a first example, consider the bipolar circuit of Fig. 12.1a. For mid-band small-signal operation about the bias point $V_{I 1}=V_{I 2}$ and $I_{C}=I_{\text {BIAS }} / 2$, the linear equivalent circuit is that shown in Fig. 12.10. Note that we have assumed that the bias current source has a finite output resistance $R_{I}$. $R_{I}$ is presumably large. Notice also that in order to obtain a symmetrical circuit, it was necessary to draw the single resistor $R_{I}$ as two resistors of value $2 R_{I}$ in parallel.

In Fig $12.11 a$ and $12.11 b$ the half-circuit models for difference and common mode input signals, respectively, are drawn for the circuit of Fig. 12.10. We are left to analyze circuits that are very familiar to us from our work in Chap. 11 with single-transistor amplifier stages. We can write by inspection that

$$
\begin{equation*}
A_{v d}=-g_{m} R_{L}^{\prime} \tag{12.32}
\end{equation*}
$$

and

$$
\begin{equation*}
A_{\nu c} \approx-\frac{R_{L}^{\prime}}{2 R_{I}} \tag{12.33}
\end{equation*}
$$




FIGURE 12.10
Small-signal mid-band linear equivalent circuit for the bipolar differential amplifier circuit of Fig. 12.1a.

(a)

(b)

FIGURE 12.11
Half-circuit models of the circuit of Fig. 12.1a and 12.10: (a) for difference mode input signals; (b) for common mode input signals.
where $R_{L}^{\prime}$ is the parallel combination of $R_{L}$ and $R_{C}$. Clearly, if $R_{I}$ is very large, $A_{v c}$ will be very small (i.e., $\ll 1$ ), whereas $A_{v d}$ will be relatively large. The common mode rejection ratio is $g_{m} R_{I}$.

Next consider the two circuits of Fig. 12.2. Half-circuit models for difference mode input signals are drawn in Fig. 12.12. The similarity of these circuits to a single-transistor stage with a degenerate-emitter stage and to a source-follower stage are clear. Again the difference mode voltage gain can be written by inspection. For the circuit in Fig. 12.12a we have

$$
\begin{equation*}
A_{\nu d} \approx-\frac{R_{L}^{\prime}}{R_{E}} \tag{12.34}
\end{equation*}
$$

and for the circuit in Fig. $12.12 b$ we have

$$
\begin{equation*}
A_{\nu d} \approx 1 \tag{12.35}
\end{equation*}
$$

You should be able to prove to yourself that the common mode voltage gain for the circuit in Fig. $12.12 a$ is $-R_{C} /\left(R_{E}+2 R_{I}\right)$ and for Fig. $12.12 b$ is approximately. 1. Perhaps surprisingly, this last common voltage gain is large, as common mode voltage gains go, but this is of no practical consequence because this stage is always used after other differential stages that have very small common mode outputs. That is, there is no common mode signal left, so passing it unattenuated does not cause any problems.


FIGURE 12.12
Half-circuit difference mode input models: (a) of the circuit in Fig. 12.2a; (b) of the circuit in Fig. 12.2b.

These few examples should offer you graphic proof that the half-circuit analysis technique greatly simplifies the problem of analyzing the small signal voltage gain performance of differential amplifiers. In the next sections we will expand our discussion to include current gains and input and output resistances and will see further evidence of the utility of the half-circuit technique.

### 12.3.3 Current Gains

We have thus far concentrated on voltage signals as the inputs and outputs to differential amplifiers. This is the way we usually think of differential amplifiers, but we could also have looked at current inputs and outputs. Our choice of voltages was based largely on convenience, as well as recognition of the fact that we usually think of the voltage drops caused by currents flowing through loads as our signals. Still, it is important to realize that an arbitrary set of input currents, $i_{i 1}$ and $i_{i 2}$, can also be written in terms of a common mode input current $i_{i c}$ and difference mode input current $i_{i d}$; that is,

$$
\begin{align*}
& i_{i 1}=i_{i c}+\frac{i_{i d}}{2}  \tag{12.36a}\\
& i_{i 2}=i_{i c}-\frac{i_{i d}}{2} \tag{12.36b}
\end{align*}
$$

where the definitions of $i_{i c}$ and $i_{i d}$ are analogous to, and consistent with, those for $v_{i c}$ and $v_{i d}$ :

$$
\begin{align*}
& i_{i c} \equiv \frac{\left(i_{i 1}+i_{i 2}\right)}{2}  \tag{12.37a}\\
& i_{i d} \equiv i_{i 1}-i_{i 2} \tag{12.37b}
\end{align*}
$$

When the common mode input current $i_{i c}$ is applied to both inputs, the output currents, $i_{o 1}$ and $i_{o 2}$, are both $i_{o c}$. When the difference mode input current $i_{i d}$ is applied to input 1 and its negative is applied to input 2, the output currents are of equal magnitude, $\left|i_{o d}\right|$, and of opposite signs (i.e., $i_{o 1}=i_{o d}$ and $i_{o 2}=-i_{o d}$ ). Using superposition, we find that the total output currents are then given by

$$
\begin{align*}
& i_{o 1}=i_{o c}+\frac{i_{o d}}{2}  \tag{12.38a}\\
& i_{o 2}=i_{o c}-\frac{i_{o d}}{2} \tag{12.38b}
\end{align*}
$$

We define a common mode current gain $A_{i c}$ and difference mode current gain $A_{i d}$ as follows:

$$
\begin{align*}
A_{i c} & \equiv \frac{i_{o c}}{i_{i c}}  \tag{12.39a}\\
A_{i d} & \equiv \frac{i_{o d}}{i_{i d}} \tag{12.39b}
\end{align*}
$$

Just as the common mode voltage gain will in general be very small for a welldesigned differential amplifier, so too will the common mode current gain. The differential mode current gain will typically be extremely large.

### 12.3.4 Input and Output Resistances

The total input (and output) resistances of a differential amplifier can be defined just as they are for any circuit in terms of the total input (or output) current and voltage. However, it is far more useful when dealing with a differential amplifier to speak in terms of a difference mode and a common mode input resistance and a difference mode output resistance, since these are the quantities of importance in most applications of these amplifiers.

The difference mode input resistance $R_{i d}$ is defined as

$$
\begin{equation*}
R_{i d} \equiv \frac{v_{i d}}{i_{i d}} \tag{12.40}
\end{equation*}
$$

and the common mode input resistance $R_{i c}$ is defined as

$$
\begin{equation*}
R_{i c} \equiv \frac{v_{i c}}{i_{i c}} \tag{12.41}
\end{equation*}
$$

Half-circuit techniques can be used to calculate these quantities. Because the half-circuit models are analogous to those of the single-transistor amplifier stages discussed in Chap. 11, you are already familiar with them. For example, for the circuits of Figs. 12.11a and $b, R_{i d}$ is $r_{\pi}$ and $R_{i c}$ is $r_{\pi}+(\beta+1) 2 R_{I}$. The latter is essentially $2 \beta R_{I}$. Looking at these two results, we see that $R_{i c}$ is clearly extremely large, whereas $R_{i d}$ is relatively much smaller.

Similarly, since the output is primarily due to the differential mode signal, it is almost exclusively the differential mode output resistance $R_{o d}$ that is of interest. This resistance is calculated using the difference mode half-circuit. The input is set equal to zero (i.e., shorted to ground), and the resistance seen looking back into the output terminals is calculated. This resistance is defined as $R_{o d}$.

For the above definition, $R_{o d}$ is the output resistance for a single-ended output, that is, when either $v_{o 1}$ or $v_{o 2}$ (or $i_{o 1}$ or $i_{o 2}$ ) is taken as the output. If the output is instead taken between both outputs (i.e., double-ended), then $v_{o}$ will be ( $v_{o 1}-v_{o 2}$ ), which is $v_{o d}$, whereas $i_{o}$ will still be $i_{o d} / 2$. Consequently the output resistance seen looking back from the two output terminals is $2 v_{o d} / i_{o d}$, or $2 R_{o d}$.

### 12.4 OUTPUTS, CURRENT MIRRORS, AND ACTIVE LOADS

A differential amplifier offers a choice of output voltages, and this matter deserves a bit of discussion. We have identified three output signals, $v_{01}, v_{02}$, and $v_{0}$. In the jargon of the field, $v_{o 1}$ and $v_{o 2}$ are called single-ended outputs. For reasons that will become obvious soon, $v_{o 1}$ is called the normal, or noninverting, single-ended output and $v_{o 2}$ is called the inverting single-ended output. In the same vein, $v_{o}$ is called the double-ended output. Notice that for the circuits we analyzed in Sec. 12.3.2 (i.e., those pictured in Figs. 12.2 and 12.10 through 12.12), we assumed that we were taking single-ended outputs.

We now want to show that these three signals are all related in a simple way if the common mode voltage gain is negligibly small, as it always is in a welldesigned differential amplifier. To see this we refer to Eqs. (12.28d) and (12.29) for $v_{o 1}$ and $v_{o 2}$, respectively. We assume that we are dealing with a well-designed circuit for which the common mode voltage gain is very small (i.e,, $A_{v c} \approx 0$ ) to obtain first from Eq. (12.28d) that

$$
\begin{equation*}
v_{o 1} \approx A_{v d} \frac{v_{i d}}{2} \tag{12.42a}
\end{equation*}
$$

which we can also write as

$$
\begin{equation*}
v_{o 1} \approx A_{v d} \frac{\left(v_{i 1}-v_{i 2}\right)}{2} \tag{12.42b}
\end{equation*}
$$

Next we see from Eq. (12.29) that $\nu_{o 2}$ can be written as

$$
\begin{equation*}
v_{o 2} \approx-A_{v d} \frac{v_{i d}}{2} \tag{12.43a}
\end{equation*}
$$

and thus

$$
\begin{equation*}
v_{02} \approx-v_{01} \tag{12.43b}
\end{equation*}
$$

or

$$
\begin{equation*}
v_{o 2} \approx-A_{v d} \frac{\left(v_{i 1}-v_{i 2}\right)}{2} \tag{12.43c}
\end{equation*}
$$

Finally, $v_{o}$ is $v_{o 1}-v_{o 2}$, so we have

$$
\begin{equation*}
v_{o} \approx 2 v_{o 1} \tag{12.44a}
\end{equation*}
$$

and thus

$$
\begin{equation*}
v_{o} \approx A_{v d} v_{i d} \tag{12.44b}
\end{equation*}
$$

or, equivalently,

$$
\begin{equation*}
v_{o} \approx A_{v d}\left(v_{i 1}-v_{i 2}\right) \tag{12.44c}
\end{equation*}
$$

Comparison of Eqs. (12.42b), (12.43c), and (12.44c) shows that all three of the signals contain identical information; $v_{o 1}$ and $v_{o 2}$ are simply $180^{\circ}$ out of phase, and the magnitude of $v_{o}$ is twice that of $v_{o 1}$ and $v_{o 2}$. You would logically choose $v_{o}$ as the output signal, all else being equal, since it appears to be larger. It usually is, but a word of caution is in order because there is a rather subtle issue that comes into play here. To see what it is, let us assume that we are interested in applying the output to the same load $R_{L}$. In the situation where we are looking at the double-ended output, this load will be connected between the two output terminals. When we draw the differential mode half-circuit, this load will become a resistor of magnitude $R_{L} / 2$ between the output node and ground (i.e., where $R_{L}$ appeared in the circuits drawn in Figs. 12.11 and 12.12), which were drawn for a single-ended output. This may mean that $A_{\nu d}$ is reduced, which is why we need to exercise caution. If we are dealing with an emitter- or source-follower stage, which is often the case when we are dealing with an output stage, $A_{v d}$ will not be reduced significantly by this change and we do indeed gain a factor of two. If we are dealing with any of the other stages, however, $A_{v d}$ will be reduced and we will not gain nearly this much.

Frequently, a grounded output is required, in which case $v_{o}$ is not a useful output. In such situations either $v_{o 1}$ or $v_{o 2}$ must be taken as the output. This can result in gain reduced by a factor of two unless something is done. One thing that can be done to regain this factor of two is to convert the double-ended output $v_{o}$ to a grounded singled-ended output using a current mirror. The current mirror circuit is illustrated in Fig. 12.13 along with a conventional common-emitter differential stage. In the conventional stage, the signal current $i$ (which equals $g_{m} v_{i d} / 2$ ) results in an output $v_{o d}$ equal to $i R_{L} R_{C} /\left(R_{L}+R_{C}\right)$. In the current mirror circuit, the currents through the two pnp transistors used as collector "resistors" are constrained to be equal by tying the bases and emitters of these two transistors together. Since the currents through the differential pair increase and decrease by $i$ (which equals $g_{m} v_{i d} / 2$ ), a current $2 i$ is forced through the load, yielding an


FIGURE 12.13
(a) Current mirror output stage; (b) a conventional single-sided output.
output $\nu_{o}$ equal to $2 i R_{L}$. The output voltage is now even more than twice as large as before since $R_{L}$ is always larger than $R_{L}$ in parallel with $R_{C}$.

If you recall our discussion of active loads in Chap. 11, you will recognize this last result as being a consequence of the fact that the current mirror also involves the use of active loads. Comparing the current mirror circuit of Fig. 12.13 with the circuit of Fig. $11.7 b$ with a pnp active load, we see that they are the same basic idea. Significantly, however, in the present differential amplifier realization the load is even more active and doubles our gain. Physically what is going on is that we are applying a signal to both the $n p n$ transistor and to the $p n p$ active load transistor, as we discussed above and as we will see again below.

As we know from our discussions in Chap. 11, the use of an active load gives us the possibility of using a very large load resistor and getting a very large gain. In such instances we need to investigate the role that the output conductances of our devices play in limiting the gain. To explore this, consider the small-signal linear equivalent circuits shown in Fig. 12.14, which correspond to the current mirror in Fig. 12.13a. Two circuits are shown, one for the left side and one for the right side of the mirror. The subscripts $n$ and $p$ refer to the $n p n$ and $p n p$ transistors, respectively. Looking first at the left-side circuit, we see that $v_{\pi p}$, which we need in the right-side circuit, is

$$
\begin{equation*}
\nu_{\pi p}=-\frac{g_{m n}\left(v_{i d} / 2\right)}{\left(g_{o n}+g_{m p}+2 g_{\pi p}+g_{o p}\right)} \approx-\frac{g_{m n}}{g_{m p}} \frac{v_{i d}}{2} \tag{12.45}
\end{equation*}
$$

where we have used the fact that $g_{o n}, g_{o p}$, and $g_{\pi p}$ are much smaller than $g_{m p}$ to simplify the expression. We see right away that the $g_{m p} v_{\pi_{p}}$ generator in the


FIGURE 12.14
Small-signal linear equivalent circuits for analysis of the current mirror circuit in Fig. 12.13a: (a) for the left side of the circuit; (b) for the right side of the circuit.
right-side circuit is proportional to $v_{i d}$; it is $-g_{m n} v_{i d} / 2$. Focusing now on the right-hand circuit, we see that we have

$$
\begin{equation*}
v_{o}=\frac{g_{m n}\left(v_{i d} / 2\right)-g_{m p} v_{\pi p}}{g_{o n}+g_{o p}+G_{L}} \approx \frac{g_{m n} v_{i d}}{g_{o n}+g_{o p}+G_{L}} \tag{12.46}
\end{equation*}
$$

Thus the differential mode voltage gain $A_{v d}$ is $g_{m n} /\left(g_{o n}+g_{o p}+G_{L}\right)$. If $R_{L}$ is relatively small and $G_{L}$ is much greater than $g_{o n}$ or $g_{o p}$, this voltage gain is just $g_{m} R_{L}$. If $R_{L}$ is large, the maximum gain will be limited by $g_{o n}$ and $g_{o p}$; our familiar $g_{m} r_{o}$ (or $g_{m} / g_{o}$ ) factor shows up again.

It is important to realize that we can use a current mirror only if we are willing to accept a single-ended output, but that is often exactly what we want and is in general no problem.

### 12.5 CURRENT SOURCE DESIGNS

In our discussion of biasing single-transistor amplifier stages in Sec.11.1.1, we saw that the quiescent collector current in a transistor can be established independently of the output and load resistance, as long as the transistor is in its forward active region. We can say this another way: in the bipolar transistor, for example, the output portion of the large-signal model (i.e., the base-collector circuit in a common-base connection or the collector-emitter circuit in common-emitter connection) is simply a current source ( $\alpha_{F} i_{F}$ or $\beta_{F} i_{B}$, respectively) that depends only on the input and not on the load. The same is true of the MOSFET; the output current in saturation is $K\left(v_{D S}-V_{T}\right)^{2} / 2$, independent of the output. $v_{D S}$. We now use this feature to get the current source $I_{\text {BIAS }}$ that we need to bias our differential pair. We will look at a number of designs, both bipolar and MOSFET.


FIGURE 12.15
Use of an $n p n$ bipolar transistor to bias a differential amplifier.

### 12.5.1 Bipolar Current Sources

We use the common-emitter configuration to make a bipolar current source because it has high current gain; we connect the collector to the coupled emitters of the differential pair as illustrated in Fig. 12.15. The voltage reference set between the emitter and base terminals sets the collector current level, as long as the transistor $Q_{B}$ is not saturated.

There are several common methods of setting the voltage reference on the base-emitter junction of this current source, just as there were when we were concerned with biasing bipolar single-transistor amplifier stages in Sec. 11.1.1. Four are illustrated in Fig. 12.16, and we will briefly discuss each below.
a) Resistive voltage divider. The resistive voltage divider is shown in Fig. $12.16 a$. Although this circuit is commonly used with single-transistor amplifiers made with discrete transistors, it is seldom used with integrated differential amplifiers because it can be readily improved upon. The improvements involve additional transistors that are expensive in discrete designs but have negligible impact on the cost of an integrated circuit.
b) Resistive voltage divider with temperature compensation. A major problem of simple resistive voltage divider biasing, Fig. $12.16 a$, is the variability and temperature sensitivity of the emitter-base voltage drop. The circuit of Fig. 12.16b


FIGURE 12.16
Several different bipolar current source designs: (a) resistive voltage divider; (b) resistive voltage divider with temperature compensation; (c) bias without emitter resistors; (d) base current compensation.
offers a ready solution by adding a matching junction to the voltage divider circuit. Adding another transistor is only a very minor complication in most integrated circuits and costs next to nothing. By using different-sized emitter resistors, different bias currents can be obtained.
c) Bias without emitter resistors. The problem with resistor biasing is that resistors consume a great deal of space on an integrated circuit and are to be avoided in general. A common solution is the circuit of Fig. 12.16c, in which the emitter resistors have been eliminated. To get different bias current levels, transistors with different emitter-base junction areas are used. For this scheme to work, however, the transistors must have identical values of $J_{E S}, J_{C S}, a_{F}$, and $a_{R}$. Although this is hard to achieve with discrete devices, such matching is routinely found in integrated circuits, and this scheme is very easy to implement.

There is a problem with this circuit, however, that has to do with its temperature stability. Since this scheme relies on identical transistors with identical values of $v_{B E}$ having identical emitter currents, it also relies on all of the transistors having the same temperature. If one of the transistors should begin to warm
up more than the others, its current will increase relative to that in the other transistors. This is so because $J_{E S}$ is very temperature-sensitive, being proportional to $n_{i}^{2}$, which in turn increases with temperature $T$ as $T^{3} e^{-E_{g} / k T}$. The increase in current will cause the affected transistor to heat up even more, causing a further increase in current, and so on. The situation snowballs, and the transistor burns itself out.

This thermal runaway event can be prevented by putting a small amount of resistance back into the emitter leg of each transistor, as we had in Figure 12.16b. Only a small resistor is needed, however (nowhere near as large as in the scheme of Fig. 12.16b): a resistance slightly larger than the effective small-signal equivalent linear emitter resistance, $k T / q\left|I_{E}\right|$, is adequate. If $\left|I_{E}\right|$ is 1 mA , for example, this is only $25 \Omega$.

To see where this last result comes from, write the emitter current in one of the transistors ( $Q 2$, for example):

$$
\begin{equation*}
\left|I_{E 2}\right|=I_{E S 2} e^{q\left(V_{\mathrm{REF}}-I_{E 2} R_{E 2}\right) / k T} \tag{12.47}
\end{equation*}
$$

Then differentiate with respect to $T$ :

$$
\begin{align*}
\frac{d\left|I_{E 2}\right|}{d T}= & \frac{\left|I_{E 2}\right|}{I_{E S 2}} \frac{d I_{E S 2}}{d T}-\left|I_{E 2}\right| \frac{q}{k T^{2}}\left(V_{\mathrm{REF}}-I_{E 2} R_{E 2}\right) \\
& +\left|I_{E 2}\right| \frac{q}{k T} R_{E 2} \frac{d\left|I_{E 2}\right|}{d T} \tag{12.48}
\end{align*}
$$

Recognizing $q\left|I_{E 2}\right| / k T$ as $g_{e 2}$ and moving the last term to the left-hand side of the equation, we have

$$
\begin{equation*}
\frac{d\left|I_{E 2}\right|}{d T}\left(1-g_{e 2} R_{E 2}\right)=\left|I_{E 2}\right|\left[\frac{1}{I_{E S 2}} \frac{d I_{E S 2}}{d T}-\frac{q}{k T^{2}}\left(V_{\mathrm{REF}}-I_{E 2} R_{E 2}\right)\right] \tag{12.49}
\end{equation*}
$$

Next, we look at $d I_{E S 2} / d T$. The main temperature dependence of $I_{E S 2}$ is through the $e^{-E g / k T}$ in $n_{i}^{2}$, and thus we have

$$
\begin{equation*}
\frac{1}{I_{E S 2}} \frac{d I_{E S 2}}{d T} \approx \frac{E_{g}}{k T^{2}} \tag{12.50}
\end{equation*}
$$

and our equation for $d I_{E S} / d T$ becomes

$$
\begin{equation*}
\frac{d\left|I_{E 2}\right|}{d T}=\frac{\left|I_{E 2}\right|}{\left(1-g_{e 2} R_{E 2}\right)} \frac{1}{k T^{2}}\left[E_{g}-q\left(V_{\mathrm{REF}}-I_{E 2} R_{E 2}\right)\right] \tag{12.51}
\end{equation*}
$$

The last factor in this equation is always positive, so the only way to guarantee that $d\left|I_{E 2}\right| / d T$ is negative is to make the term $\left(1-g_{e 2} R_{E 2}\right)$ negative. This occurs when $R_{E 2}$ is greater $1 / g_{e 2}$ (i.e., $K T / q\left|I_{E 2}\right|$ ).
d) Base current compensation. A shortcoming of all of the circuits illustrated thus far is that they assume negligible base current. At times, such as when one reference transistor is used to establish the base-emitter voltages on many current sources, this is not a good assumption and a circuit such as that illustrated in

Fig. $12.16 d$ is used. In this circuit an additional transistor $Q_{1}$ has been added to provide the base currents, and the imbalance is reduced by a factor of $\beta_{F}$.
e) Very low bias levels. The current sources in Fig. 12.16 would all require very large value resistors to yield bias currents in the microampere range; producing such large resistors is difficult in an integrated circuit. At the same time, it is sometimes desirable to have such low bias levels because this results in a large $r_{\pi}$ and thus in a larger input resistance to a bipolar transistor stage. An interesting solution to this problem is the Widlar current source illustrated in Fig. 12.17. This circuit was invented by one of the early "gurus" of analog integrated circuit design, Robert J. Widlar, and is used, for example, in the 741 operational amplifier to bias the input stage.

To analyze the Widlar current source, we begin by calculating the current through the reference transistor, $I_{\text {REF }}$. Assuming that the transistors are identical, high- $\beta$ devices and that $V_{B E, \mathrm{ON}}$ is approximately 0.6 V , we have

$$
\begin{equation*}
I_{\mathrm{REF}} \approx \frac{\left(V_{C C}+V_{E E}-0.6 \mathrm{~V}\right)}{R_{1}} \tag{12.52}
\end{equation*}
$$

Next we move on to calculating $I_{\text {BIAS }}$, but we immediately note that if we assume $V_{B E, \text { ON }}$ is 0.6 V for both transistors, we will find that $I_{\mathrm{BIAS}}$ is zero, since summing voltages around the lower loop yields

$$
\begin{equation*}
V_{B E 1}=V_{B E 2}+R_{2} I_{\mathrm{BIAS}} \tag{12.53}
\end{equation*}
$$

Clearly we must be more careful and cannot make this assumption at this stage of the calculation. Rather we must use the Ebers-Moll model. Assuming that both transistors are identical, have high gain, and are biased in their forward active region, we obtain

$$
\begin{equation*}
V_{B E 1} \approx \frac{k T}{q} \ln \frac{I_{\mathrm{REF}}}{I_{E S}} \tag{12.54}
\end{equation*}
$$



FIGURE 12.17
Widlar current source, a design used when relatively small bias currents are needed.

$$
\begin{equation*}
V_{B E 2} \approx \frac{k T}{q} \ln \frac{I_{\mathrm{BIAS}}}{I_{E S}} \tag{12.55}
\end{equation*}
$$

Combining the last three equations gives us a transcendental equation for $I_{\mathrm{BIAS}}$ :

$$
\begin{equation*}
I_{\mathrm{BIAS}}=\frac{k T}{q R_{2}} \ln \frac{I_{\mathrm{REF}}}{I_{\mathrm{BIAS}}} \tag{12.56a}
\end{equation*}
$$

This looks messy at first, but remember that as a circuit designer you know the values of $I_{\text {BIAS }}$ and $I_{\text {REF }}$ you want to achieve and that what you need to calculate is the required value of $R_{2}$. Thus this equation should instead be written as it will be used:

$$
\begin{equation*}
R_{2}=\frac{k T}{q I_{\mathrm{BIAS}}} \ln \frac{I_{\mathrm{REF}}}{I_{\mathrm{BIAS}}} \tag{12.56b}
\end{equation*}
$$

As a numerical example, assume we want $I_{\text {REF }}$ to be 1.0 mA and choose $I_{\text {BIAS }}$ to be $10 \mu \mathrm{~A}$. We calculate $R_{2}=11.5 \mathrm{k} \Omega$. For comparison, a design like that of Fig. $12.16 c$ or $d$ would require an emitter resistor in excess of $200 \mathrm{k} \Omega$, a prohibitively high value to realize on an integrated circuit.
f) Voltage compliance. The range of output voltages over which a current source can operate is called its voltage compliance; this is an important characteristic of any given current source design. In the designs in Figs. 12.16 and 12.17, the relevant voltage is that on the collector of the current source transistor, say $Q_{2}$, relative to the negative supply $V_{E E}$. The largest this voltage can be will be determined by the breakdown voltage of the transistor, in this case $Q_{2}$. The smallest it can be will be set by saturation of the same transistor; in designs without any emitter resistors, such as those in Figs. $12.16 c$ and $d$, the output can go to within a few tenths of a volt of $-V_{E E}$. In the other designs, the output must be kept higher by an amount corresponding to the voltage drop across the relevant emitter resistor. This is a good argument for keeping the emitter resistor as small as practical in light of other considerations (see Sec.12.5.1c above).

### 12.5.2 MOSFET Current Sources

MOSFET current source topologies are analogous to those in Figs. 12.16a, b, and $c$ (and you should be able to easily sketch and analyze them). The same comments concerning their relative merits apply to the MOSFET versions of these circuits as applied to the bipolar circuits. Note that there is no need for a MOSFET equivalent to the bipolar circuit with base current compensation, Fig. 12.16d, because there is no gate current and thus no need to compensate for any imbalance it would cause. In an integrated circuit context, the MOSFET equivalent of the circuit of Fig. $12.16 c$ is the most attractive because integrated resistors are relatively large and space-consuming and transistors are small, readily available, and closely matched. This MOSFET current source circuit is illustrated in Fig. 12.18. As is shown in this figure, different current levels are obtained by suitably adjusting the width-to-length ratios of the MOSFET gate regions. In practice, the


FIGURE 12.18
MOSFET current source design commonly used in integrated circuits.
gate length $L$ is usually held fixed and the gate width $W$ is varied from device to device.

The choice of whether to use a bipolar or a MOSFET current source in a given circuit usually depends on what type of integrated circuit-bipolar or MOS-is being built. That is, we often do not have a choice. In some cases, however, such as in discrete designs (which are extremely rare these days) or in processes yielding both BJTs and MOSFETs, we have an option and the need to choose does arise. In such situations, BJTs are preferred for several reasons. The most important is that a bipolar current source will have a larger voltage compliance; that is, it will tolerate a wider voltage swing on its output terminal without coming out of its forward active region: $v_{C E}$ can be as small as 0.2 V , whereas $v_{D S}$ has to be at least ( $v_{G S}-V_{T}$ ), which is typically a volt or more. This results in a larger voltage compliance and, consequently, a larger common mode voltage range. Another reason to prefer BJT current sources is that BJTs tend to have larger output resistances than MOSFETs and thus look more nearly like ideal current sources. MOSFETs do have one advantage; they do not have a gate current and thus there is no need to compensate for the imbalance caused by the nonzero base current in a BJT.

The problem of the lower output resistance of MOSFETs can be serious when we have to use a MOSFET current source, so ways have been developed to improve upon this aspect of the basic MOSFET current source shown in Fig. 12.18. An example is shown in Fig. 12.19a, in which a second layer of transistors has been added, yielding a cascode-like* connection with significantly enhanced output resistance. The analysis of this circuit is relatively straightforward. The

[^17]

FIGURE 12.19
(a) MOSFET current source design that overcomes the problem of the relatively low output resistance often encountered in MOSFETs. (b) The input resistance test circuit; (c) The resulting incremental equivalent circuit.
incremental output resistance is measured by setting all independent voltage sources to zero, except for a test voltage $v_{t}$ applied to the output terminals, and by determining the current $i_{t}$. If you refer to the input resistance test circuit in Fig. 12.19b and its incremental equivalent circuit in Fig. 12.19c when you perform the analysis of this circuit, you will find that the output resistance is given by

$$
\begin{equation*}
R_{\mathrm{out}}=r_{o}\left[2+r_{o}\left(g_{m}+g_{m b}\right)\right] \tag{12.57a}
\end{equation*}
$$

(In arriving at this result we have assumed that the output resistances of all of the transistors in the circuit are the same.) Using the fact that we can also write $g_{m b}$ as $\eta g_{m}$, we have

$$
\begin{equation*}
R_{\text {out }}=r_{o}\left[2+r_{o} g_{m}(1+\eta)\right] \tag{12.57b}
\end{equation*}
$$

This is to be compared with an output resistance for the circuit of Fig. 12.18 of simply $r_{0}$. The output resistance is thus increased by a factor of more than $r_{0} g_{m}$, which as we discussed in Sec. 11.4.1 $a$, can be quite significant. Recalling Eq. (11.51), this factor can be written as $2\left|V_{A} /\left(V_{G S}-V_{T}\right)\right|$; thus if $\left|V_{A}\right|$ is on the order of 30 V and the numerator is 1.5 V , this will be a factor of 40 . If we can be comfortable biasing even closer to $V_{T}$, a choice that depends on our process control, we can make it even larger.

Notice that adding a second layer of transistors means that this circuit has a lower voltage compliance than the circuit in Fig. 12.18. By the same token, it also reduces the common mode voltage swing of any stage biased using this scheme, so this is not necessarily a good circuit for use on an input stage. On later stages common mode voltage swing is no longer a concern; as will become clear in the next chapter.

### 12.6 SUMMARY

In this chapter, as in most of this text, there is something basic and general you should learn, and there are numerous smaller and more specific things you should learn-the forest and the trees, as it were. In this case the "forest" is the concept of symmetry and the power of invoking symmetry to simplify an analysis. The "trees" are the specifics and properties of differential amplifier and current source circuits.

Symmetry is a very powerful tool that is used to advantage in many disciplines. In this chapter we have used symmetry to argue that certain nodes in a symmetrical linear circuit with differential mode inputs must be at zero potential and thus are incremental grounds. We have also argued that the current in links that connect the two halves of a symmetrical circuit with common mode inputs must be zero and that these links thus are functionally open circuits. Finally, we have argued on the basis of symmetry that corresponding signals on either side of a symmetrical circuit are either of equal magnitude and sign or of equal magnitude but opposite sign, respectively, for common mode or difference mode inputs. The net result has been a tremendous simplification of our problem. Identifying certain nodes as grounded and/or certain links as open simplifies the circuit. Furthermore, recognizing that the answers for one half of a circuit trivially gives us those for the other half cuts our remaining work in half, all because we stopped to think about the problem before we attacked it.

The specific conclusions we have reached in this chapter about differential amplifiers are also very important. We have seen that these circuits are ideally perfectly symmetrical and that they are typically biased using current sources. They have two input signals, and the output can be taken in several ways (i.e., either from the two separate output terminals or as the difference between the signals on these two terminals). We have shown that it is possible to decompose any arbitrary pair of inputs into a common mode input and a difference mode input, and we have seen that a differential amplifier responds primarily only to difference mode inputs (it responds quite well, in fact, and the
differential input voltage of an emitter-coupled pair must be less than $k T / q$ to maintain linear operation). Common mode inputs, on the other hand, have almost no effect on the output of the differential amplifier, as long as they are not so positive or negative that they drive the circuit out of its linear active region. It is safe to say that this sensitivity to differential mode inputs and insensitivity to common mode inputs is the most important practical feature of differential amplifiers.

To aid our analysis, we have used symmetry to introduce the concept of half-circuit models and thereby greatly simplify our analyses. With this step, we have found that our circuit models became identical to those we had analyzed in our study of single-transistor linear amplifier stages, circuits with which we are already quite familiar.

Finally, we have studied several designs for current source circuits, which are used to bias differential amplifiers. The circuits we have looked at range from the very simple and rather sensitive (to device and temperature variations), to the more complex and more robust. These circuits, in fact, represent a very nice set with which to begin to understand some of the issues a circuit designer working with real physical devices must consider; and they are worth reviewing in this light. There are many circuits that can do a particular job, but not all designs are good designs. In rare cases, circuit designs with improved performance and insensitivity to device and environmental variations can be implemented at very modest cost in terms of realizing them as an integrated circuit (the format we usually encounter in modern design). However, many designs-which for the most part we do not discuss-are impractical to implement.

## PROBLEMS

12.1 All of the transistors in the differential amplifier circuit illustrated in Fig. P12.1 are identical with $\beta_{f}=100, v_{B E, \mathrm{ON}}=0.7 \mathrm{~V}$, and $v_{C E, S A T}=0.2 \mathrm{~V}$.
(a) What are the quiescent collector currents in these transistors when $v_{I 1}=v_{I 2}=$ 0 ?
(b) What is the largest positive value of pure common mode voltage that can be applied to the input terminals without driving the transistors into saturation?
(c) What is the largest negative value of pure common mode voltage that can be applied to the input terminals without driving the transistors into cutoff?
(d) What is the differential mode voltage gain of this circuit?
(e) What is the differential mode input resistance of this circuit?
12.2 In the circuit in Fig. P12.2a, all the transistors are identical with $\beta=500, v_{B E, \mathrm{ON}}=$ 0.6 V , and $r_{x}$ (the base resistance other than $r_{\pi}$ ) $=0$. Use reasonable approximations in your solution.
(a) Specify the values of $I_{1}$ and $R_{1}$ necessary to achieve an operating point of $I_{C Q}=$ 1 mA for each transistor and zero offset on the output (i.e., $v_{\text {OUT }}=0$ when $\nu_{\mathrm{IN}}=0$ ).
(b) Determine the open-circuit $\left(R_{L} \rightarrow \infty\right)$ mid-band voltage gain of the circuit.
(c) Determine the mid-band voltage gain when $R_{L}=1 \mathrm{k} \Omega$.


FIGURE P12.1
(d) If the current source $I_{1}$ is to be realized through the circuit in Fig. P12.2b, determine the appropriate value for $R_{2}$.
12.3 The circuit parameters for the circuit in Fig. P12.3 are as follows:

$$
\begin{aligned}
I & =2 \mathrm{~mA} \\
k T / q & =0.025 \mathrm{~V} \\
R_{L} & =2 \mathrm{k} \Omega \\
R_{E} & =1 \mathrm{k} \Omega \\
R_{O} & =10^{6} \Omega \\
V & =6 \mathrm{~V}
\end{aligned}
$$



FIGURE P12.2a
FIGURE P12.2b


FIGURE P12.3

The hybrid- $\pi$ parameters are as follows:

$$
\begin{aligned}
r_{b} & =0 \\
C_{\pi} & =2 \mathrm{pf} \\
C_{\pi} & =3 \mathrm{pf} \\
g_{m} & =q I_{C} / k T \\
g_{\pi} & =g_{m} / \beta \\
\beta & =100
\end{aligned}
$$

(a) For the circuit illustrated above, draw the small-signal incremental half-circuit models valid for (i) differential mode input, and (ii) common mode input.
(b) Calculate the mid-band differential mode voltage gain.
(c) Calculate the mid-band common mode voltage gain.
12.4 Consider the BiMOS differential amplifier circuit illustrated in Fig. P12.4. (BiMOS means the circuit contains both bipolar and MOS devices.) The pnp transistors have a forward beta $\beta_{F}$ of 50 and Early voltage $V_{A}$ of 20 V . The base-emitter voltage $V_{B E}$ is -0.6 V in the forward active region, and the transistors saturate when the emittercollector voltage $V_{E C}$ is less than 0.2 V . The $n p n$ transistors have a forward beta $\beta_{F}$ of 100 and Early voltage of -60 V . The base-emitter voltage $V_{B E}$ is 0.6 V in the forward active region, and the transistors saturate when the collector-emitter voltage $V_{C E}$ is less than 0.2 V . The $n$-channel MOSFETs have a $K$-factor of $100 \mu \mathrm{~A} / \mathrm{V}^{2}$, threshold voltage $V_{T}$ of 1.0 V , and Early voltage $V_{A}$ of 10 V .
(a) Select $R$ to yield a quiescent collector current in $Q_{6}$ of 0.1 mA . (Assume that $Q_{5}$ and $Q_{6}$ are identical transistors.)
(b) With $R$ as in part a and with $v_{\mathrm{IN} 1}=v_{\mathrm{IN} 2}=0$, what is the gate-to-source voltage $V_{G S}$ on $Q_{3}$ ?
(c) What is the maximum possible common mode input voltage for which the transistors will be operating in their forward active regions?

(d) What is the mid-band small-signal output resistance of this amplifier?
(e) The mid-band small-signal open-circuit difference-mode voltage gain of this stage, $A_{\nu d, o c}$, is a function of $I_{C 6}$, the quiescent collector current of $Q_{6}$. Does $A_{v d, o c}$ increase, decrease, or remain essentially unchanged if $I_{C 6}$. is increased? Support your answer by explicitly stating the functional proportionality between $A_{v d, o c}$ and $I_{C 6}$.
12.5 The emitter-coupled amplifier shown in Fig. P12.5a contains identical transistors $Q_{1}$ and $Q_{2}$, which have the following characteristics:

$$
\begin{aligned}
V_{B E, \mathrm{ON}} & =0.6 \mathrm{~V} \\
V_{C E, \mathrm{SAT}} & =0.2 \mathrm{~V} \\
\beta_{F} & =200
\end{aligned}
$$

The amplifier is driven by the ideal incremental voltage sources $v_{i 1}$ and $v_{i 2}$.
Notice that this amplifier is resistively biased, not current source biased.
(a) With $R_{1}=1 \mathrm{k} \Omega$, and $R_{2}=1.2 \mathrm{k} \Omega$, verify that with $v_{I 1}=v_{I 2}=0$ the transistors are operating in their forward active region.
(b) With $R_{2}=1.2 \mathrm{k} \Omega$ and $v_{I 1}=v_{I 2}=0$, how large can $R_{1}$ be before the transistors cease to operate in their forward active region?
The circuit is modified as shown in Fig. P12.5b by connecting a resistor $R_{3}$ between the two output terminals.
(c) With $R_{1}=1 \mathrm{k} \Omega$ and $R_{2}=2 \mathrm{k} \Omega$, the amplifier is driven by a pure difference mode incremental signal $v_{i 1}=-v_{i 2}=v_{i d} / 2$. Evaluate the incremental voltage gain $v_{o 2} / v_{i d}$. Give your answer first in literal (symbolic) form and then in numerical form.
(d) Repeat part c when the amplifier is driven by a pure common mode incremental signal $v_{i c}=v_{i 1}=v_{i 2}$ (i.e., find $v_{o 2} / v_{i c}$ ).


## FIGURE P12.5a

12.6 Consider the design of a series of three MOSFET current sources providing $0.1,0.2$, and 0.3 mA , respectively. The circuit is shown in Fig. P12.6.

Each MOSFET has the same gate length $L$, which is $1 \mu \mathrm{~m}$, but they may have different widths $W$. All have the same threshold voltage $V_{T}$, which is 1.0 V . For the reference transistor $Q_{R}, W$ is $200 \mu \mathrm{~m}$ and $K$ is $0.12 \mathrm{~mA} / \mathrm{V}^{2}$.
(a) Select a value for the quiescent drain current of $Q_{R}$ and values for $W_{1}, W_{2}$, and $W_{3}$. Assume that you want to minimize the size of devices in this current source.


FIGURE P12.5b


FIGURE P12.6
(b) What value should $R_{R}$ have to get the quiescent drain current you designed in part a?
(c) Assuming that the Early voltage $V_{A}$ of $Q_{R}$ is 20 V , what is $V_{A}$ for $Q_{1}, Q_{2}$, and $Q_{3}$ ? (Note: You will have to reason for yourself how $V_{A}$ should vary with $W$.)
(d) Using your results in part c , calculate the mid-band incremental linear output resistance of each of the three current sources. Notice that this is just $1 / g_{o}$ for the relevant transistor, that is, of $Q_{1}, Q_{2}$, and $Q_{3}$, respectively.
12.7 This question concerns the design of the differential amplifier circuit pictured Fig. P12.7a. The box labeled "Output stage" will be described in more detail later; for parts a through c you may assume that it has infinite input resistance. The transistors


FIGURE P12.7a


FIGURE P12.7b
are npn bipolar transistors with $\beta=100$; in their hybrid- $\pi$ models $r_{x}$ is zero and $g_{o}$ is given by $I_{C} / V_{A}$, where $V_{A}=50 \mathrm{~V}$.
(a) Draw a small-signal linear equivalent circuit for the input stage suitable for calculating $v_{\text {mid }} / v_{\text {in }}$. Clearly label the values of $r_{\pi}, g_{m}, g_{0}$, etc.
(b) Derive an expression for the mid-band incremental voltage gain of the first stage, $\nu_{\text {mid }} / v_{\text {in }}$.
(c) What is the maximum common mode input voltage $v_{C}$ that can be applied to this amplifier without affecting its operation?
Next consider the two possible topologies of the output stage box illustrated in Fig. P12.7b.
(d) Suppose that you want each of these output stages to be capable of delivering $\pm 2 \mathrm{~V}$ to a $1-\mathrm{k} \Omega$ load. What is the maximum value the resistor $R$ can have, and what is the corresponding quiescent collector current in $Q_{2}, I_{C 2}$, in each circuit?
12.8 Consider the four input device/active load combinations illustrated in Fig. P12.8. If $I_{\text {BIAS }}$ can range between $10 \mu \mathrm{~A}$ and 1 mA , find the optimum bias level for each combination to achieve the following:
(a) Maximum differential mode voltage gain at output (open circuit)
(b) Maximum input resistance
(c) Maximum output resistance
(d) Largest positive common mode input voltage limit
(e) Largest negative common mode input voltage limit
12.9 For each of the following input signal voltage pairs, calculate the common mode and difference mode voltages.


FIGURE P12.8
(a) $v_{\mathrm{IN} 1}=6 \mathrm{~V}, v_{\mathrm{IN} 2}=3 \mathrm{~V}$
(b) $v_{\mathbb{N} 1}=5 \sin \omega t \mathrm{~V}, v_{\mathrm{IN} 2}=0$
(c) $v_{\mathrm{IN} 1}=\left(r \sin \omega t+3 \sin \omega_{2} t\right) \mathrm{V}$
$v_{\mathrm{IN} 2}=3 \sin \omega_{2} t \mathrm{~V}$
(d) $v_{\mathrm{IN} 1}=5 \cos (\omega t+\theta) \mathrm{V}$
$v_{\mathrm{IN} 2}=5 \cos \omega t \mathrm{~V}$

## MULTISTAGE AMPLIFIERS

The single-transistor circuits discussed in Chap. 11 and the differential amplifier circuits discussed in Chap. 12 can be used as building blocks to assemble more complex amplifier circuits. Through the careful selection and combination of building-block circuits, or "stages," it is possible to design circuits that have levels of gains and combinations of input and output resistances unattainable from single stages. These multistage circuits will be our subject in this chapter.

An important consideration in the design of multistage amplifiers is how the individual stages interact and influence the characteristics of their neighbors. As we shall see, the output of any given stage will be the input to the succeeding stage, and the input resistance of any given stage will be the load seen by the stage preceding it. It is essential that individual stages be selected and combined with these interactions taken into account.

Another important consideration, and perhaps the most difficult challenge encountered when combining two or more transistors into a complex circuit like a multistage amplifier, is to simultaneously bias all of the transistors in the circuit in their forward active region without compromising the performance of any of the individual stages. Each of the approaches to multistage amplifiers we will study in this chapter handles this problem in a different way.

We will begin in the next section by considering an old, relatively primitive, yet powerful approach to combining multiple stages: the capacitively coupled cascade. Then we will look at more sophisticated directly coupled stages, and finally we will discuss differential amplifiers, an important class of multistage amplifiers built up primarily of differential-pair stages.

### 13.1 CAPACITIVELY COUPLED CASCADE

The simplest solution to the problem of combining and biasing several transistor stages is to couple them using capacitors. The capacitors are open circuits to the bias voltages and currents, so the biases on the individual stages are unaffected by combining the stages in this way. At the same time, if the capacitors are large enough, they will look like short circuits to the time-varying signals to be amplified, as you will recall from our discussion of the concept of mid-band frequencies in Sec. 11.2. Coupling stages one after another is termed cascading, and doing so via capacitors like this creates what is called a capacitively coupled cascade.

An example of two common-emitter stages coupled capacitively is shown in Fig. 13.1 $a$. The capacitor $C_{C}$ is used to couple the output of the first stage to the input of the second; clearly the bias points are not changed by coupling them in this way.

The mid-band small-signal linear equivalent circuit for the circuit in Fig. $13.1 a$ is drawn in Fig. 13.1b. Again we are interested in the voltage, current, and power gains of this circuit, as well as its input and output resistances.


FIGURE 13.1
(a) Two common-emitter stages coupled capacitively via $C_{C}$; (b) the corresponding mid-band small-signal linear equivalent circuit ( $R_{B 1}$ is the parallel combination of $R_{B 11}$ and $R_{B 21}$, and $R_{L 1}$ is the parallel combination of $R_{C 1}, R_{B 12}$, and $R_{B 22}$ ).

A little thought shows us that the voltage gain $A_{v}$ is just the product of the voltage gains of the individual stages. To see this, define the voltage gains of the first stage, $A_{\nu 1}$, and of the second stage, $A_{\nu 2}$, as follows:

$$
\begin{align*}
A_{\nu 1} & \equiv \frac{v_{\text {out } 1}}{v_{\text {in }}}  \tag{13.1a}\\
A_{\nu 2} & \equiv \frac{v_{\text {out }}}{v_{\text {in } 2}} \tag{13.1b}
\end{align*}
$$

Since $v_{\text {in } 2}$ is identical to $v_{\text {out }}$, we have immediately that

$$
\begin{equation*}
A_{\nu 1} A_{\nu 2}=\frac{v_{\mathrm{out}}}{v_{\mathrm{in}}} \equiv A_{v} \tag{13.2}
\end{equation*}
$$

The issue now is to calculate the voltage gain of each stage. Looking at the first stage, we see that the load on this stage is the parallel combination of the stage-one collector resistor, the stage-two base bias resistors, and $r_{\pi 2}$ (i.e., $\left.R_{C 1}\left\|R_{B 12}\right\| R_{B 22} \| r_{\pi 2}\right) . A_{\nu 1}$ is thus given by

$$
\begin{equation*}
A_{\nu 1}=-g_{m 1}\left(R_{C 1}\left\|R_{B 12}\right\| R_{B 22} \| r_{\pi 2}\right) \tag{13.3a}
\end{equation*}
$$

Because $r_{\pi 2}$ will typically be the smallest of these resistors, it is frequently true that this reduces to

$$
\begin{equation*}
A_{\nu 1} \approx-g_{m 1} r_{\pi 2} \tag{13.3b}
\end{equation*}
$$

For the second stage we have

$$
\begin{equation*}
A_{v 2}=-g_{m 2} R_{L 2}^{\prime} \tag{13.4}
\end{equation*}
$$

where, as before, $R_{L 2}^{\prime}$ is defined as the parallel equivalent of $R_{C 2}$ and $R_{L}$.
The total mid-band voltage gain is thus approximately

$$
\begin{equation*}
A_{\nu} \approx g_{m 1} g_{m 2} r_{\pi 2} R_{L 2}^{\prime} \tag{13.5a}
\end{equation*}
$$

Recognizing the product $r_{\pi 2} g_{m 2}$ as $\beta_{F 2}$ we can write $A_{y}$ as

$$
\begin{equation*}
A_{\nu} \approx g_{m 1} \beta_{F 2} R_{L 2}^{\prime} \tag{13.5b}
\end{equation*}
$$

Writing the voltage gain in this way, we see immediately that the magnitude of the gain of this two-stage cascade is $\beta_{F 2}$ times as large as that of a similar single-stage amplifier.

The current and power gains are also the products of the gains of the individual stages and can be calculated just as easily. The input and output resistances of this cascade are the same as the input and output resistances of the first and second stage, respectively.

Cascading two common-emitter stages gives us more gain than we can achieve with a single stage, as we have seen; this is a common reason for going to a multistage design. Another reason for combining multiple stages is to obtain independent control over the input and output resistances and the gain. It is often desirable, for example, to have an amplifier with a very low output resistance. This can be accomplished by using an emitter-follower as the last stage. The input resistance of a follower stage is large, so it also does not reduce the voltage gain of the preceding stages. It is an excellent final, or "output," stage.

It may also be desirable to have a high input resistance in an amplifier, in which case a degenerate-emitter or degenerate-source stage can be used as the first stage. If, on the other hand, a low input resistance is needed, a common-base or common-gate stage should be used as the input stage.

## Example

Question. Consider the capacitively coupled three-stage bipolar amplifier with a common-base input stage, a common-emitter gain stage, and an emitter-follower output stage shown in Fig. 13.2a. Assume that this circuit is designed to be used in an application where its input resistance is matched to that of the source; also assume that $R_{T}$ is $50 \Omega$. Derive approximate expressions for the mid-band voltage gain and the mid-band input and output resistance for this amplifier. The transistors have current gains $\beta_{F}$ of 80 .

Discussion. Based on what we know about the individual stages used to assemble this amplifier, we anticipate that it will have low input and output resistances and


FIGURE 13.2
(a) Three-stage capacitively coupled amplifier having a low-input-resistance common-base first stage, a high-gain common-emitter second stage, and a low-output-resistance emitter-follower final stage; $(b)$ the mid-band incremental equivalent model.
a large mid-band voltage gain. To see if this is indeed the case, we first determine the mid-band small signal equivalent circuit; this is shown in Fig. 13.2b. In this circuit we have defined $R_{B 1}$ as $R_{C 1}\left\|R_{B 12}\right\| R_{B 22}$ and $R_{B 2}$ as $R_{C 2}\left\|R_{B 13}\right\| R_{B 23}$. Base bias resistors are typically 10 to 100 times as large as collector resistors, so we expect that $R_{B 1}$ is approximately equal to $R_{C 1}$ and $R_{B 2}$ is approximately $R_{C 2}$.

The input and output resistances are the easiest to calculate. The input resistance is $R_{E 1} \| r_{e 1}$; since $R_{E 1}$ is typically several $\mathrm{k} \Omega$, the only way this will be as small as $50 \Omega$ is if $r_{e 1}$ is the dominant term. That is, we want $r_{e 1} \ll R_{E 1}$ so that

$$
\begin{equation*}
R_{\mathrm{in}} \approx r_{e 1}=50 \Omega \tag{13.6}
\end{equation*}
$$

From Eq. (8.62), $r_{e 1}$ is approximately $k T / q I_{C 1}$, so to have an $R_{\text {in }}$ of $50 \Omega$ we need a bias level $I_{C 1}$ of 2 mA .

This circuit indeed has a small input resistance. It is so small in fact that we should ask if our model is adequate and, in particular, if there are parasitic elements we have neglected that we should include. In this case it is the base resistance $r_{x}$ we may want to consider. It is of the same magnitude as $r_{e 1}$ (i.e., 25 to $50 \Omega$ ), and it is positioned between the intrinsic base terminal and ground. Fortunately, however, in this position $r_{x}$ looks from the input like an even smaller resistor that is, $(1-\alpha) r_{x}$; and thus it has essentially no effect on $R_{\text {in }}$ (you should take the time to convince yourself of this).

The output resistance [see Eq. (11.48)] is $R_{E 3}$ in parallel with $\left(r_{\pi 3}+R_{B 2}\right)$ divided by $\left(\beta_{F}+1\right)$; that is,

$$
\begin{equation*}
R_{\text {out }}=R_{E 3} \| \frac{\left(r_{\pi 3}+R_{B 2}\right)}{\left(\beta_{F}+1\right)} \tag{13.7a}
\end{equation*}
$$

Since all of these resistors are of comparable magnitude, the latter factor will clearly dominate. Thus we have

$$
\begin{equation*}
R_{\mathrm{out}} \approx \frac{\left(r_{\pi 3}+R_{C 2}\right)}{\beta_{F}} \tag{13.7b}
\end{equation*}
$$

where we have also made use of the facts that all of the transistor values of $\beta_{F}$ in this circuit are identical and much greater than 1 and that $R_{B 1}$ is approximately $R_{C 2}$. The value of $r_{\pi 3}$ is typically several kilo-ohms, and we expect $R_{C 2}$ to be several kilo-ohms as well. Thus $R_{\text {out }}$ will be $100 \Omega$ or less, which is indeed low as output resistances go, as we expected it would be.

Turning next to the voltage gain, we can easily write an exact expression for $A_{\nu}$, but this will be unnecessarily complicated. It is easier to assume we have a well-designed circuit and to develop an approximate solution that might allow us more insight. (We should, of course, check our assumptions once we finish.)

We expect, for example, that the voltage gain of the emitter-follower stage is approximately 1 . Thus we have

$$
\begin{equation*}
v_{\text {out }} \approx-g_{m 2} v_{\pi 2} R_{B 2} \tag{13.8}
\end{equation*}
$$

We also have

$$
\begin{equation*}
v_{\pi 2}=g_{m 1} v_{e} \frac{R_{B 1} r_{\pi 2}}{\left(R_{B 1}+r_{\pi 2}\right)} \tag{13.9}
\end{equation*}
$$

and

$$
\begin{equation*}
v_{e} \approx v_{\mathrm{in}} \frac{r_{e 1}}{\left(r_{e 1}+R_{T}\right)} \tag{13.10}
\end{equation*}
$$

Combining these three expressions to obtain the overall mid-band voltage gain, we find

$$
\begin{equation*}
A_{\nu} \approx-\frac{g_{m 1} g_{m 2} r_{e 1} R_{B 1} R_{B 2} r_{\pi 2}}{\left(R_{B 1}+r_{\pi 2}\right)\left(r_{e 1}+R_{T}\right)} \tag{13.11a}
\end{equation*}
$$

At this point we have an expression, but we still don't know much about the voltage gain. To see what this expression says, we begin by pointing out that the product $g_{m 2} r_{\pi 2}$ is $\beta_{F}$. We could similarly note that the product $g_{m 1} r_{e 1}$ is approximately 1 , but rather than use this relationship we instead note that a lowresistance input like that of this circuit is typically used, as it is here, to achieve matching to a source; that is, $R_{\text {in }}\left(\approx r_{e 1}\right)=R_{T}$. Thus the factor $r_{e 1} /\left(r_{e 1}+R_{T}\right)$ can be expected to be on the order of $\frac{1}{2}$. It certainly won't be any smaller than this, and the largest it can be is 1 ; in this example we have been told to select $r_{e 1}$ so that it is exactly $\frac{1}{2}$. Simialrly, the factor $R_{B 1} /\left(R_{B 1}+r_{\pi 2}\right)$ will also be on the order of $\frac{1}{2}$ since $R_{B 1}$ and $r_{\pi 2}$ will be of the same order of magnitude (i.e., several kilo-ohms).

Using all of these observations in our expression for the gain, we obtain

$$
\begin{equation*}
A_{v} \approx-\frac{\beta_{F} g_{m 1} R_{B 2}}{4} \tag{13.11b}
\end{equation*}
$$

This starts to look like something we can appreciate. It looks almost like $\beta_{F} / 4$ times the gain of a single common-emitter gain stage, $-g_{m} R_{L}$, except, of course, that the transconductance and load correspond to different stages. Notice that $g_{m 1}$ is directly related to $R_{\mathrm{in}}$, so its maximum value is already constrained by the input resistance specified in this example. Similarly, $R_{B 2}$ plays a major role in determining $R_{\text {out }}$, so if there had been a constraint on $R_{\text {out }}$ in this example, the size of $R_{B 2}$, and thus the magnitude of the maximum voltage gain, would have been largely predetermined.

Another way to look at the voltage gain is in terms of performance measures such as input and output resistances and maximum voltage swings. To do this, note first that in a common-base stage, $g_{m 1}$ equals $1 / r_{e 1}$, and in this circuit this is essentially $1 / R_{\text {in }}$. Then note that $R_{B 2}$ is approximately $R_{C 2}$, which can be written as $\Delta v_{\text {out }} / I_{C 2}$, where $\Delta v_{\text {out }}$ is the magnitude of the maximum positive output voltage swing; this is limited by the bias on the collector of $Q_{2}$. Using these equivalents in Eq. 13.11b, we arrive at

$$
\begin{equation*}
A_{\nu} \approx-\frac{\beta_{F}}{4} \frac{\Delta v_{\mathrm{out}}}{I_{C 2} R_{\mathrm{in}}} \tag{13.11c}
\end{equation*}
$$

Again we see that our only real design option is to reduce $I_{C 2}$. Of course, as we do this, we must also increase $R_{C 2}$ to keep the voltage drop across it at $\Delta v_{\text {out }}$ or more, and as we increase $R_{C 2}$, our approximation that $R_{B 2}$ is effectively just $R_{C 2}$ starts to suffer. One way or another, there is a limit to how small we can make $I_{C 2}$, and thus on how large $A_{\nu}$ can be.

Notice, finally, that the input stage contributes significantly to the overall voltage gain, along with the so-called gain stage. There is nothing wrong with this, of course, and the more benefit we can get from the individual stages, the better. Strictly speaking, perhaps, we should call the first stage an input-gain stage in this case, but this is not usually done.

Capacitively coupled cascades are easy to design but use many passive elements (i.e., capacitors and resistors). Although this is not a significant problem for circuits made by soldering individual ("discrete") components together, it is a major problem for integrated circuits. Putting large capacitors in an integrated circuit is difficult because they would occupy large areas of the silicon chip. As such, capacitively coupled circuits cannot be economically integrated. They are simply not practical, so alternatives must be found. Another shortcoming of capacitively coupled circuits is that they have a limited mid-band frequency range. In particular, they are not useful at low frequencies unless very large coupling capacitors are used, which becomes prohibitive, even for circuits made of discrete components. The solution is to go to direct coupling (i.e., coupling without the use of capacitors). We will examine doing this in the next two sections, beginning in Sec. 13.2 with direct-coupled single-transistor stages and ending in Sec. 13.3 with direct-coupled differential pairs.

### 13.2 DIRECT-COUPLED AMPLIFIERS

If the bias levels on two successive capacitively coupled stages are selected so that the quiescent voltage across the coupling capacitor is zero, then the capacitor can be removed and the two terminals connected without disturbing the bias of either stage. The two stages are then said to be direct-coupled. It is clear that we have less freedom in selecting the biases on the individual stages of a directcoupled multistage amplifier because the bias levels must match in this way, but this may be a small price to pay to eliminate the coupling capacitors. It also turns out, as we shall see shortly, that we can also often eliminate a significant number of resistors through direct coupling, which is also important, especially in an integrated circuit.

The input and output coupling capacitors can also be eliminated if two supply voltages are used. We have already seen two supplies being used to bias a MOSFET in Sec. 11.1.2, and two supplies can similarly be used with bipolar amplifiers. Then, if the biasing is designed so that the quiescent voltage on the input and output terminals is 0 V , the input and output can be directly coupled to the signal source and load, respectively. We will see an example of this next in Sec. 13.2.1.

We will look at directly coupling specific combinations of single-transistor stages in the rest of this section. We will find that there are limits to how far we can go with this scheme and that we must work hard to eliminate all of the bias capacitors. In Sec. 13.3 we will see how differential pairs let us overcome these final limitations.

### 13.2.1 Direct-Coupled Cascade

Imagine that in the amplifier in Fig. 13.1 the bias is such that the voltage on the collector of the first transistor and that on the base of the second transistor are identical, and thus there is no voltage drop across the coupling capacitor $C_{C}$. This capacitor can then be removed, leaving us with the circuit of Fig. 13.3a. When


FIGURE 13.3


FIGURE 13.3 (Continued)
Direct-coupled versions of the amplifier in Fig. 13.1: (a) the coupling capacitor has been removed; ( $b$ ) the redundant resistors have also been removed; $(c)$ two sources have been used to also permit direct coupling of the input and output; (d) the circuit of (c) has been modified with a level-shift stage placed after gain stages to achieve a quiescent output voltage Vout of 0 V ; (e) the circuit has been further modified by using a current source to bias the level-shift stage, so that the gain of this stage is unity, by adding an emitter-follower output stage and by eliminating the emitter capacitors.
you look at this circuit it should be clear to you that the base bias resistors $R_{B 12}$ and $R_{B 22}$ are also superfluous and can be removed without changing the bias point of either transistor. Doing this yields the circuit of Fig. 13.3b. This circuit is an example of a direct-coupled cascade of two common-emitter stages.

Other combinations of single-transistor stages can also be direct-coupled and cascaded in this same fashion with similar reductions in the number of biasing
resistors and elimination of coupling capacitors. We will look at more examples in the next three subsections.

Before moving on, however, we should also consider the possibility of eliminating the input and output capacitors. To do this we must first use two bias supplies, $+V_{C C}$ and $-V_{E E}$, as shown in Fig. 13.3c. A bit of work with this example, however, shows that it is impossible to bias both the input and the output terminal to 0 V and still be able to have more than $\pm 0.4 \mathrm{~V}$ swing of the output signal. The solution is to add a follower output stage that also shifts the output down to 0 V. Such a stage, which is called a level-shift stage, is shown in Fig. 13.3d. The problem with this stage, though, is that its gain is less than 1 because the output is taken off a voltage divider. The solution to this problem is to replace the lower resistor with a current source as shown in Fig. 13.3e, in which an emitter-follower has also been added at the output to reduce the output resistance.

In the circuit in Fig. 13.3e, the last capacitors, namely those in the emitters of $Q_{1}$ and $Q_{3}$, have also been removed. The circuit can now realistically be integrated, but since the gain stages are now degenerate-emitter stages rather than common-emitter stages, the overall gain is much lower. This, unfortunately, is the price that must be paid in order to eliminate emitter capacitors when cascading single-transistor stages. Only by using emitter-coupled pair stages, as we shall do in Sec. 13.3, is it possible to have high-gain common-emitter stages without using emitter capacitors.

### 13.2.2 Cascode

The cascode is a direct-coupled cascade combination that is important enough to have its own name. It is a direct-coupled common- or degenerate-emitter (or -source) stage followed by a common-base (or common-gate) stage. A capacitively coupled bipolar version of this is shown in Fig. 13.4a. To directly couple these two stages we connect the emitter of the second stage to the collector of the first, as in Fig. 13.4b, so that the same collector current flows through both transistors. We also obtain the base biases from a single three-resistor voltage-divider chain. In this way we eliminate three resistors and the coupling capacitor between the two stages. We cannot eliminate any more of the capacitors, however, even if we use two bias supplies. The more common way of drawing the bipolar cascode is shown in Fig. 13.4c.

This combination of stages might seem a bit strange to you at first because using a low-input-resistance common-base circuit as the load on a degenerateemitter or common-emitter stage ensures that the voltage gain of the first stage will be very low. The first stage will, however, still have a current gain of $\beta_{F}$; since the common-base stage will provide a voltage gain of $g_{m} R_{L}^{\prime}$, the combination of the two stages turns out (see below) to have roughly the same overall mid-band characteristics as the first stage alone, so nothing is lost. In fact, a great deal is actually gained, but this does not become clear until one analyzes the highfrequency performance of the cascode, as we shall do in Chap. 14. What we


FIGURE 13.4
Cascode configuration: (a) a capacitively coupled common-emitter and common-base pair; (b) the cascode, a direct-coupled common-emitter and common-base pair; (c) the cascode circuit of (b) redrawn in the form typically used to draw the cascode.
find is that the high-frequency mid-band limit, $\omega_{\mathrm{HI}}$, is considerably higher for the cascode than it is for the first stage alone.

To examine the mid-band performance of the cascode, we draw the smallsignal equivalent circuit of the bipolar cascode in Fig. 13.5. Notice that the small-signal model of Fig. $8.25 b$ has been used for $Q_{2}$, the transistor in the common-base stage. This is not essential to the analysis, but it does simplify it considerably. (You may want to go through the analysis using the hybrid- $\pi$ model for $Q_{2}$ to see for yourself; it is good practice and builds character, too.) Notice that the voltage gain of the first stage, $v_{e b 2} / v_{\pi 1}$, is $-g_{m} / g_{e}$, or $-\left(\beta_{F}+1\right) / \beta_{F}$, which is essentially -1 . The voltage gain of the second stage, $v_{\text {out }} / v_{e b 2}$, is, however, $g_{m} R_{L \prime}$, so the overall gain is $-g_{m} R_{L \prime}$, just as it is in a similarly biased and loaded common-emitter stage. In terms of current gain, the current gain of the first stage is $g_{m} / g_{\pi}$, or $\beta_{F}$, whereas the current gain of the second is $\beta_{F} /\left(\beta_{F}+1\right)$, which is $\alpha_{F}$, or essentially 1 . Once again the overall current gain $\beta_{F}$ is the same as that of the common-emitter stage.

A MOSFET cascode is pictured in Fig. 14.10, and a similar mid-band analysis is done for it there. In Chap. 14 we also look at the high-frequency performance of the cascode, which, as we shall see, is where the real value of this topology becomes evident.

### 13.2.3 Darlington

A very common direct-coupled combination is an emitter-follower first stage followed by a common-emitter or a degenerate-emitter second stage. The capacitively coupled version of such a combination is shown in Fig. 13.6a, and the directcoupled version is shown in Fig. 13.6b. Notice that the high input resistance sought from the emitter-follower stage is enhanced by biasing it at a very low collector current, which makes its $r_{\pi}$ large.

The composite of two transistors connected as in Fig. $13.6 b$ is called a Darlington pair. It looks a great deal like a single transistor with a current gain $\beta^{\prime}$ that is essentially the product of the $\beta \mathrm{s}$ of the two individual transistors in the pair, with an emitter-base "on" voltage of 1.2 V , and with a large incremental input resistance. To see these features we will first look at the large-signal behavior of a


FIGURE 13.5
Mid-band incremental equivalent circuit for the bipolar cascode pictured in Fig. $13.4 c$.


FIGURE 13.6
(a) Capacitively coupled emitter-follower stage and common-emitter stage; (b) the direct-coupled version (the last combination of two transistors is called a Darlington pair).

Darlington pair and then look at a mid-band small-signal linear equivalent circuit model. To examine the large-signal behavior, consider the large-signal equivalent circuit in Fig. 13.7a, which we obtain by simply replacing the two transistors of the pair by their forward-active-region large-signal models. This model can be simplified to that illustrated in Fig. $13.7 b$ by a suitable choice of element values. To begin with, $V_{B E, O N}$ of the composite device must clearly be 1.2 V . Next notice that the base current of the second transistor, $i_{B 2}$, is $\left(\beta_{1}+1\right) i_{B 1}$. Thus the collector current $i_{C}^{\prime}$ of the composite structure is $\beta_{1} i_{B 1}+\beta_{2}\left(\beta_{1}+1\right) i_{B 1}$, and the equivalent current gain $\beta^{\prime}$ is given by

$$
\begin{equation*}
\beta^{\prime}=\beta_{1} \beta_{2}+\beta_{1}+\beta_{2} \tag{13.12}
\end{equation*}
$$

which is approximately $\beta_{1} \beta_{2}$ if $\beta_{1}$ and $\beta_{2}$ are large.
To consider the small-signal linear circuit behavior of a Darlington pair, assume that both members of the pair are biased in their forward active region


FIGURE 13.7
Large-signal circuit models for a Darlington pair based in its forward active region: (a) the circuit obtained by modeling the two individual transistors using hybrid- $\phi$-like model for the composite Darlington transistor.
and draw the equivalent circuit illustrated in Fig. 13.8a, where we have used the mid-band hybrid- $\pi$ models for the two transistors. We want to find an equivalent circuit for the composite device like that shown in Fig. 13.8b. Focusing first on Fig. 13.8a, we note that since $I_{B 2}$ is $\left(\beta_{1}+1\right) I_{B 1}$ (see above and Fig. 13.7a), $r_{\pi 2}$ is equal to $r_{\pi 1} /\left(\beta_{1}+1\right)$. This has two consequences. First, because the base signal current $i_{b 2}$ of $Q_{2}$ is $\left(\beta_{1}+1\right) i_{b 1}$, where $i_{b 1}$ is the base signal current of $Q_{1}$, the two voltage drops $v_{\pi 1}$ and $v_{\pi 2}$ (which are, respectively, $r_{\pi 1} i_{b 1}$ and $r_{\pi 2} i_{b 2}$ ) turn out to be the same (i.e., $v_{b^{\prime} e^{\prime}} / 2$ ). Second, the input resistance of the composite device is $r_{\pi 1}+\left(\beta_{1}+1\right) r_{\pi 2}$, and because $r_{\pi 2}$ is $r_{\pi 1} /\left(\beta_{1}+1\right)$, this sum is simply $2 r_{\pi 1}$. Thus in Fig. $13.8 b$ we have

$$
\begin{gather*}
r_{\text {in }} \equiv r_{\pi}^{\prime}=2 r_{\pi 1}  \tag{13.13}\\
v_{b^{\prime} e^{\prime}} \equiv v_{\pi}^{\prime}=2 v_{\pi 1} \tag{13.14}
\end{gather*}
$$

Proceeding, we short-circuit the output and note that the collector current $i_{c}^{\prime}$. of the composite device is the sum of the two individual transistors' collector currents, $i_{c 1}$ and $i_{c 2}$, so we must have

$$
\begin{equation*}
i_{c}^{\prime}=g_{m 1} v_{\pi 1}+g_{m 2} v_{\pi 2} \tag{13.15a}
\end{equation*}
$$

which, using the fact that $v_{\pi 1}$ and $v_{\pi 2}$ are equal, is

$$
\begin{equation*}
i_{c}^{\prime}=\left(g_{m 1}+g_{m 2}\right) v_{\pi 1} \tag{13.15b}
\end{equation*}
$$



FIGURE 13.8
Small-signal mid-band linear equivalent circuit models for a Darlington pair: (a) the circuit obtained by modeling the two individual transistors using hybrid- $\pi$ models; (b) a hybrid- $\pi$-like model for the composite Darlington transistor.
or

$$
\begin{equation*}
i_{c}^{\prime}=\left(g_{m 1}+g_{m 2}\right) \frac{v_{e^{\prime} b^{\prime}}}{2} \tag{13.15c}
\end{equation*}
$$

We define the factor $\left(g_{m 1}+g_{m 2}\right) / 2$ as $g_{m}^{\prime}$. Then clearly

$$
\begin{equation*}
g_{m}^{\prime}=\frac{q\left(I_{C 1}+I_{C 2}\right)}{2 k T} \tag{13.16a}
\end{equation*}
$$

which in terms of the quiescent collector current $I_{C}^{\prime}$ of the composite device is

$$
\begin{equation*}
g_{m}^{\prime}=\frac{q I_{C}^{\prime}}{2 k T} \tag{13.16b}
\end{equation*}
$$

This is a relationship with which we are familiar, except that there is now a factor of 2 in the denominator. This factor comes from the fact that we now have two transistors and the input voltage is split equally between them.

The only factor for which we do not yet have a practical expression is $r_{\pi}^{\prime}$. There are various ways to obtain the expression we seek, but a convenient one is to note that we must have

$$
\begin{equation*}
g_{m}^{\prime} v_{\pi}^{\prime}=\beta^{\prime} i_{b}^{\prime} \tag{13.17}
\end{equation*}
$$

and also that

$$
\begin{equation*}
v_{\pi}^{\prime}=r_{\pi}^{\prime} i_{b}^{\prime} \tag{13.18}
\end{equation*}
$$

Combining these two equations yields

$$
\begin{equation*}
r_{\pi}^{\prime}=\frac{\beta^{\prime}}{g_{m}^{\prime}} \tag{13.19}
\end{equation*}
$$

which is another relationship with which we are familiar from our earlier work.
If we compare a Darlington pair with a single transistor biased such that the Darlington and the transistor have the same $g_{m}$, the input resistance of the Darlington pair is roughly $\beta$ times larger than that of the single transistor. Getting a large input resistance in a bipolar transistor circuit is the motivation for using the Darlington connection.

Next we consider the output resistance of the Darlington connection. Imagine setting $v_{b^{\prime} e^{\prime}}$ to zero and applying a test voltage $v_{t}$ between $c^{\prime}$ and $e^{\prime}$. We want to calculate the resulting current $i_{t}$ that flows into $c^{\prime} ; r_{o}^{\prime}$ will be $v_{t} / i_{t}$. First, summing the currents at node $c^{\prime}$, we will have

$$
\begin{equation*}
i_{t}=g_{o 2} v_{t}+g_{m 2} v_{\pi 2}+\left(v_{t}-v_{\pi 2}\right) g_{o 1}+g_{m 1} v_{\pi 1} \tag{13.20a}
\end{equation*}
$$

Noting that since $\nu_{b^{\prime} e^{\prime}}$ is zero, we have $\nu_{\pi 1}=-v_{\pi 2}$, and regrouping terms, we can write this as

$$
\begin{equation*}
i_{t}=\left(g_{o 1}+g_{o 2}\right) v_{t}+\left(g_{m 2}-g_{m 1}-g_{o 1}\right) v_{\pi 2} \tag{13.20b}
\end{equation*}
$$

Next, summing currents at the node between $r_{\pi 1}$ and $r_{\pi 2}$ (i.e., at the emitter of $Q_{1}$ ), we find

$$
\begin{equation*}
\left(g_{\pi 1}+g_{m 1}\right) v_{\pi 1}+g_{o 1}\left(v_{t}-v_{\pi 2}\right)-g_{\pi 2} v_{\pi 2}=0 \tag{13.21a}
\end{equation*}
$$

which, again using $v_{\pi 1}=-v_{\pi 2}$ and regrouping, becomes

$$
\begin{equation*}
v_{\pi 2}=\frac{g_{o 1} v_{t}}{g_{m 1}+g_{\pi 1}+g_{\pi 2}+g_{o 1}} \tag{13.21b}
\end{equation*}
$$

This can now be combined with Eq. (13.20b) to obtain

$$
\begin{equation*}
\frac{i_{t}}{v_{t}}=g_{o}^{\prime}=g_{o 2}+g_{o 1}+\frac{\left(g_{m 2}-g_{m 1}-g_{o 1}\right) g_{o 1}}{g_{m 1}+g_{\pi 2}+g_{\pi 1}+g_{o 1}} \tag{13.22a}
\end{equation*}
$$

Looking first at the last term in this expression, the sum in parentheses in the numerator is essentially $g_{m 2}$ because $g_{m 2}$ is by far the largest term (assuming a reasonable output resistance). In the denominator, $g_{\pi 1}$ is clearly much less than $g_{m 1}$, and $g_{o 1}$ should also be negligible. At the same time, $g_{\pi 2}$ and $g_{m 1}$ are essentially equal and are $\beta_{2}$ times smaller than $g_{m 2}$. The denominator is thus effectively $2 g_{m 2} / \beta_{2}$, and the entire last term in Eq. (13.22a) is approximately $\beta_{2} g_{o 1} / 2$, so we have

$$
\begin{equation*}
g_{o}^{\prime} \approx g_{o 2}+\frac{\beta_{2} g_{o 1}}{2} \tag{13.22b}
\end{equation*}
$$

Finally, recalling that $g_{o 1}$ can be written in terms of the Early voltage and bias point as $I_{C 1} /\left|V_{A 1}\right|$, that $g_{o 2}$ can be written as $I_{C 2} /\left|V_{A 2}\right|$, and that $\beta_{2} I_{C 1}$ is approximately $I_{C 2}$, we find that Eq. (13.22b) can also be written as

$$
\begin{equation*}
g_{o}^{\prime} \approx g_{o 2}\left(1+\frac{\left|V_{A 2}\right|}{2\left|V_{A 1}\right|}\right) \tag{13.22c}
\end{equation*}
$$

If the Early voltages of $Q_{1}$ and $Q_{2}$ are equal we have simply that

$$
\begin{equation*}
g_{0}^{\prime} \approx 1.5 g_{02} \tag{13.22d}
\end{equation*}
$$

The bottom line is that the output conductance is larger and the output resistance is smaller, and this is not good. Fortunately, there is an easy fix to this problem. By leaving the collector of $Q_{1}$ connected to the power supply line as it was originally in Fig. $13.6 a$ and as shown in Fig. 13.9, rather than connecting it to the collector of $Q_{2}$ as in Fig. 13.6b, we recover our original output conductance; that is, $g_{o}^{\prime}$ becomes $g_{o 2}$. You should be able to see this by referring to Fig. 13.8a: The collector of $Q_{1}$ will now be incrementally grounded, so when we short the input and apply our test voltage, we have $v_{\pi 1}=v_{\pi 2}=0$ and $i_{t}=g_{o 2} v_{t}$. Our conclusions about $r_{\text {in }}^{\prime}$ and $g_{m}^{\prime}$ are, for all practical purposes, unchanged in this new connection.

Before leaving the Darlington we should make two final points. First, because the first transistor in the pair, $Q_{1}$, is biased at a very low current level, the $\beta$ of this transistor may be lower than that of $Q_{2}$ because of beta fall-off due to space-charge layer recombination (see Sec. 8.1.7d and Fig. 8.14). Second, although you have no way of knowing it yet, the high-frequency behavior of the Darlington connection is poorer than that of a single transistor (we discuss high-frequency performance in Chap. 14). A solution to both of these problems can be found by reinserting a resistor $R_{E 1}$ between the emitter of the first transistor and ground and by connecting the collector of the first transistor $Q_{1}$ to the power supply as we did in the previous paragraph. Both of these changes are illustrated


FIGURE 13.9
Improved Darlington connection, which is superior to the classical Darlington pair illustrated in Fig. $13.6 b$ in terms of its output resistance, transconductance, and dynamic response.
in Fig. 13.9 (which you will notice starts to look a lot like our original connection in Fig. 13.6a).

We have already discussed the impact that tying the collector of $Q_{1}$ to the supply has on the output conductance, and in Chap. 14 we will discuss its effect on the high-frequency performance. Turning then to the resistor $R_{E 1}$, adding this resistor means that the bias level of $Q_{1}$, the first transistor, can be increased. This in turn means that $Q_{1}$ is less likely to be biased where its current gain is low and, more importantly, that there will be more current available to charge and discharge the capacitive charge stores associated with the base of $Q_{2}$; the pair will have much better high-frequency performance. We will analyze this and quantify the impact of $R_{E 1}$ in Chap. 14, Sec. 14.2.7.

Another important plus of adding the resistor $R_{E 1}$ is that the transconductance of the stage is increased. Simply put, because the input resistance of the first transistor is reduced, a greater fraction of the input signal appears at the input of the second transistor. Now $v_{\pi 2}$ is greater than $v_{\pi 1}$, so more of the signal is applied to the base $Q_{2}$, the transistor with the higher transconductance. The cost of adding this resistor is that the input resistance of the stage will be reduced somewhat. We have

$$
\begin{equation*}
r_{\text {in }}=r_{\pi 1}+\left(\beta_{1}+1\right)\left(r_{\pi 2} \| R_{E 1}\right) \tag{13.23}
\end{equation*}
$$

Because $R_{E 1}$ is usually much smaller than $r_{\pi 2}$ and because $r_{\pi 1}$ will now be much smaller than previously and, if $R_{E 1}$ is doing its job, much less than $\left(\beta_{1}+1\right) r_{\pi 2}$, this is approximately

$$
\begin{equation*}
r_{\mathrm{in}} \approx\left(\beta_{1}+1\right) r_{\pi 2} \tag{13.24}
\end{equation*}
$$

This input resistance is roughly a factor of only two smaller than before, so it will still be very large.

Clearly the circuit topology in Fig. 13.9 represents a superior way to use the Darlington concept in high-performance circuit design.

### 13.2.4 Emitter/Source-Coupled Cascode

In the cascode circuit we saw that the combination of a stage with a large voltage gain and unity current gain, following a stage with large current gain but unity voltage gain, had both large current and large voltage gain. In this regard the combination looked identical to a common-emitter (or common-source) stage. (In terms of its high-frequency response, on the other hand, the cascode is far superior to the common-emitter/common-source, as we shall see in Chap. 14.)

Another similar combination of stages is an emitter-follower/source-follower stage followed by a common-base/common-gate stage, as illustrated in Fig. 13.10 using BJTs. Again, the first stage provides current gain and the second voltage gain. The overall result in terms of mid-band gain is similar to a single-transistor common-emitter/common-source stage; the attractiveness of this stage lies in its high-frequency performance, just as in the case of the cascode. You might also expect the BJT version of this combination to have a very large input impedance because of the common-emitter input, but as we shall see, this is not necessarily the case.


FIGURE 13.10
Capacitively coupled amplifier composed of an emitter-follower stage followed by a common-base stage.

There are several ways to realize a direct-coupled version of this pairing. One is shown in Fig. 13.11a. This circuit, which is called the emitter-coupled cascode, uses a pnp transistor for the second stage, and the two transistors then end up in series. The two diodes, $D_{1}$ and $D_{2}$, establish the bias point of $Q_{1}$ and $Q_{2}$, and how this is done merits a bit of discussion. $D_{1}$ is formed by connecting together the base and collector of a transistor that is identical to $Q_{1}$, and $D_{2}$ is formed in the same way from a transistor identical to $Q_{2}$ (an example of a transistor connected as a diode in this way can be found in Fig. 16.3c). These two diodes therefore have the same saturation currents, $I_{S 1}$ and $I_{S 2}$, respectively, as the base-emitter junctions of the corresponding transistors (i.e., $I_{E S 1}$ and $I_{E S 2}$ ). Thus when the diodes and transistors are connected together as they are in this circuit, the magnitude of the emitter currents, $I_{E 1}$ and $I_{E 2}$, will be the same as the magnitude of the current through the two diodes; this current is approximately $\left(V_{C C}-1.2\right) /\left(R_{B 1}+R_{B 2}\right)$. This is another example of a situation we often encounter where we can use a break-point model in certain parts of an analysis, but must use exponential diode models for other parts (other examples arose in Chap. 12 when we discussed the design of current sources). Here we are able to assume that the voltage drop across a forward-biased silicon junction is approximately 0.6 V for purposes of estimating the current through the diodes, whereas for purposes of biasing the transistors we have to remember that this is only an approximation and that the diode currents really depend exponentially on the junction voltages. Thus if we are careful to match the saturation currents and applied junction voltages of the devices, we can easily establish the desired bias levels. It is also important to recognize that we are not required to have the same quiescent current through the diodes and transistors; if the junction areas in the diodes differ from those of the


FIGURE 13.11
(a) Emitter-coupled cascode, a direct-coupled version of the circuit in Fig. 13.10 that uses an npn transistor in the emitter-follower stage and a pnp in the common-base stage; (b) the incremental equivalent circuit.
transistors, the currents will differ by the same ratio, since it is really the junction saturation current densities we are matching.

The incremental equivalent circuit is shown in Fig. 13.11b. There are several important observations we can make about this circuit. First, the input resistance is only $r_{\pi 1}+\left(\beta_{F 1}+1\right) r_{e 2}$, which is much less than you might have expected. The problem is that the resistance in the emitter circuit of the emitter-follower stage is only the input resistance of the common-base stage, which is small. It appears at the input multiplied by $\left(\beta_{F 1}+1\right)$, but that still only increases it to $r_{\pi 1}$. The input resistance of this stage is thus approximately $2 r_{\pi 1}$, or only twice that of a comparably biased common-emitter stage.

The other thing to note is that the mid-band voltage gain of this amplifier is given by

$$
\begin{equation*}
A_{\nu}=\frac{\beta_{F 1}+1}{\beta_{F 1}+\beta_{F 2}+2} g_{m 2} R_{L} \tag{13.25}
\end{equation*}
$$

There is no minus sign, and the stage is noninverting. Also, the factor $\left(\beta_{F 1}+1\right)$ / $\left(\beta_{F 1}+\beta_{F 2}+2\right)$ is on the order of 0.5 . It is usually a bit larger than 0.5 because the current gain of the $n p n, \beta_{F 1}$, can be expected to be two to three times larger than that of the $p n p, \beta_{F 2}$, but it is always less than 1 ; thus the magnitude of the mid-band voltage gain is always somewhat lower than that of a comparably biased common-emitter stage. This is the price that must be paid for the superior high-frequency performance of this stage.

A differential amplifier version of the emitter-coupled cascode is used as the input stage of the 741 operational amplifier. We will briefly consider this integrated circuit and see a schematic for it in Sec. 13.3.

Another direct-coupled version of this combination of stages can be realized using all the same types of active devices (e.g., npn BJTs), as illustrated in Fig. 13.12a. The interesting thing about this circuit is that it is essentially one we have already spent an entire chapter on (Chap. 12) without pointing out that it could be viewed as a direct-coupled pair. That is, the emitter-coupled pair can be thought of as having its origins in a direct-coupled cascade of an emitter-follower followed by a common-base stage, as shown in Fig. 13.12a. Using a current source to bias both transistors and a little imagination to see the symmetry and the possibilities of having two inputs and a differential output, we have the emitter-coupled pair of Fig. 13.12b, and of Chap. 12.

### 13.2.5 Complementary Output

The use of an emitter-follower output stage on a multistage amplifier, as was done in the circuit illustrated in Fig. 13.3e, makes good sense because it has a high input resistance, even when the load resistance is small, so it does not degrade the performance of the preceding stage by "loading" it with a low resistance to ground. It also has a voltage gain of essentially 1 , so it doesn't reduce the overall gain appreciably; and it has a relatively low output resistance, so it can be connected to a low-resistance load without significant loss of signal.

At the same time, however, the emitter-follower does have limitations when used as an output stage in an amplifier like that pictured in Fig. 13.3e, and it can be improved upon by adding to it a second, complementary stage. To see why this is so, consider the limitations on $\left|v_{\text {out }}\right|$ in the circuit of Fig. 13.3e. The first place to look is in the last gain stage, $Q_{2}$. To maximize $\left|\nu_{\text {out }}\right|$, the collector of $Q_{2}$ should be biased midway between the maximum voltage it can reach, which is $V_{C C}$, and the minimum voltage it can have, which will be roughly 0 V , assuming $V_{\mathrm{IN}}$ is 0 V and $Q_{1}$ is biased near saturation. With $Q_{2}$ biased in this way, $\left|v_{\text {out }}\right|_{\text {max }}$ will be $V_{C C} / 2$, unless it is limited even more severely by the level-shift or output stages.


FIGURE 13.12
(a) Direct-coupled cascade of the circuit in Fig. 13.10, an emitter-follower stage followed by a common-base stage, that uses all npn transistors; (b) the emitter-coupled pair.

In the positive direction, $\nu_{\text {out }}$ can be increased (by driving more current through the load $R_{L}$ and through $R_{E 4}$ ) until the collector of $Q_{2}$ is at $V_{C C}$ without any problem. At this point $v_{\text {out }}$ will be $+V_{C C} / 2$, so the last two stages do not limit the positive excursion of $v_{\text {out }}$.

In the negative direction, $v_{\text {out }}$ will be its most negative when the transistor $Q_{4}$ is nearly cut off and when the only current flowing through $R_{E 4}$ is that coming from ground through $R_{L}$ and through $R_{E 4}$, to $-V_{E E}$. Of course, the larger this current through $R_{L}$ is, the more negative $v_{\text {out }}$ will be, but this depends on $R_{E 4}$.

That is, the current in question is $V_{E E} /\left(R_{E 4}+R_{L}\right)$, and thus the minimum $v_{\text {out }}$ is $-R_{L} V_{E E} /\left(R_{E 4}+R_{L}\right)$. To get the full $\pm V_{C C} / 2$ range that we said $Q_{2}$ allowed us, we must have this be $-V_{C C} / 2$. If, as is typically the case, $V_{C C}=V_{E E}$, this says that we must have $R_{E 4} \leq R_{L}$.

Making $R_{E 4}$ this small may not seem like a big deal until we look at the implications of doing so for the quiescent power dissipation and the efficiency of this output stage. With $R_{E 4}=R_{L}$, and assuming $V_{\text {OUT }}=0$, the quiescent collector current in $Q_{4}$ is $V_{E E} / R_{L}$. The quiescent power dissipation in the output stage is therefore equal to $\left(V_{C C}-V_{E E}\right)^{2} / R_{E 4}$, or with $V_{C C}=V_{E E}, 4 V_{C C}{ }^{2} / R_{L}$. For comparison, the maximum power that will be delivered to the load is $\left(\left|v_{\text {out }}\right|_{\text {max }}\right)^{2} / R_{L}$, or $V_{C C}^{2} / 4 R_{L}$ if, as we have said, $\left|v_{\text {out }}\right|_{\text {max }}$ is $V_{C C} / 2$. Thus with this circuit the quiescent power dissipation is an alarming 16 times greater than the peak signal power delivered to the load! A more realistic comparison would actually be to assume a sinusoidal signal and to look at the average power delivered to the load; on this basis the efficiency is even worse!

To see a possible solution to this problem, recall that in the positive excursion we simply turned the output transistor $Q_{4}$ "on" more strongly, and its quiescent collector current was not an issue; it could have been as low as we wanted and we still could have gotten our desired positive swing. What is needed is another stage in parallel with the first that does the same thing for the negative swing. Such a stage is a pnp emitter-follower; an output stage with a directly coupled pair of emitter-followers, one $n p n$, and the other $p n p$, is illustrated in Fig. 13.13a. Notice that each of these stages requires a different amount of level-shifting and that this difference is conveniently provided by two forward-biased $p-n$ diodes. Notice also that now both stages can be biased at low quiescent current levels because when $v_{\text {out }}$ is positive, $Q_{4}$ is turned on more strongly and supplies, or "pushes," the needed current to $R_{L}$ from $V_{C C}$, whereas when $v_{\text {out }}$ is negative, $Q_{4}$ turns off but $Q_{5}$ turns' on more strongly and draws, or "pulls," the necessary current through $R_{L}$ to $-V_{E E}$. Because the stage operates with low quiescent current levels, the quiescent power dissipation is low. The value of bias current that is set in a given circuit will depend in large part on the output resistance sought.

A little consideration of the circuit in Fig. 13.13a will show you that $R_{E 4}$ and $R_{E 5}$ can be eliminated and that the two output transistors can be connected in series as shown in Fig. 13.13b. This direct-coupled complementary pair (i.e., an npn and a pnp) is called a complementary, or a push-pull, output stage.

The two diodes used to provide the necessary $1.2-\mathrm{V}$ level shift between the bases of $Q_{4}$ and $Q_{5}$ are often obtained by using the base-emitter junctions of two transistors identical to $Q_{4}$ and $Q_{5}$ with their base-collector junctions shorted. This provides precisely the right voltage drop and in fact ensures that the magnitude of the quiescent collector currents in $Q_{4}$ and $Q_{5}$ will be $I_{L S}$ (see the discussion of the circuit in Fig. 13.11a for a detailed explanation of this point).

Now the maximum negative excursion on $v_{\text {out }}$ is determined either by saturation of $Q_{5}$ or by the circuit used to realize the current source $I_{L S}$. That is, the


FIGURE 13.13
(a) Output of the amplifier of Fig. $13.3 e$ modified by the addition of a pnp emitter-follower; (b) simplified version of this same complementary output pair, called a complementary output stage.
node connected to the base of $Q_{5}$ is very likely tied to the collector of a transistor in the current source that will saturate if $v_{\text {out }}$ is too negative.

### 13.3 MULTISTAGE DIFFERENTIAL AMPLIFIERS

Because they are insensitive to common mode input voltages, emitter-coupled pair, or differential, stages are extremely easy to couple directly, in marked contrast to what we have found for single-transistor stages. As long as the quiescent output voltage of a stage falls within the common-mode input voltage range of the following stage, the two stages can be directly coupled; it is as simple as that.

An example of a multistage differential amplifier made of the differential-pair-stage equivalents of the single-transistor stages used in the circuit in Fig. $13.3 e$ is shown in Fig. 13.14. Note that the gain stages are slightly different in these two circuits because in Fig. $13.3 e$ we had to use degenerate-emitter stages to eliminate the final capacitors, the emitter capacitors. Now, however, with differential-pair stages we can achieve common-emitter performance without having to use emitter capacitors, and thus we can again use higher-gain commonemitter gain stages.

Although this amplifier is now a perfectly reasonable circuit, it is unlikely that it would be built exactly like this because there are numerous improvements that can still be made to it. Some are well beyond what we should be concerned with in an introductory text such as this, but others make use of tricks, known in the trade as "tools," that we already know.


FIGURE 13.14
Differential amplifier version of the multistage amplifier with two common-emitter gain stages discussed in Sec. 13.2 and illustrated in Fig. 13.3e.

First, we can increase the input resistance, which is always a desirable goal in a differential amplifier, by replacing $Q_{1}$ with either a Darlington pair or a MOSFET.

Second, we can reduce the quiescent power dissipation and increase the efficiency by using a push-pull output stage.

Third, it is often the case that we want a single-ended rather than a differential output. In this case we could leave out the left-hand member of the second differential pair.

Finally, we know that we can significantly increase our gain if we use a current mirror on a gain stage to convert to a single-ended output. In the first place, we get a much larger gain by using an active load, and, second, using the current mirror adds another factor of two to the gain.

An additional benefit of using a current mirror is that we can improve the output voltage swing and further increase the gain when putting the current mirror in the first stage by using a pnp common-emitter gain stage with a current source load as the second stage. The amplifier resulting from all of these improvements is shown in Fig. 13.15.

The increase in input resistance, the increase in the voltage gain, and the reduction in the quiescent power dissipation achieved by these changes should


FIGURE 13.15
Differential amplifier of Fig. 13.14 modified by making $Q_{1}$ a MOSFET, adding a current mirror to the first stage, making the second stage a pnp common-emitter stage with a current source load, and using a push-pull output stage.
be clear to you in light of our earlier discussions in this chapter, but the issue of the increased output voltage swing merits some discussion. Now the collector of $Q_{2}$ can be as positive as $V_{C C}+0.2 \mathrm{~V}$ before it saturates, so $v_{\text {out }}$ can be as large as $\left(V_{C C}+0.2-0.6-0.6\right)$, or $\left(V_{C C}-1 \mathrm{~V}\right)$. In the negative direction, the collector of $Q_{2}$ can go negative until the current source $I_{\text {BIAS2 }}$ saturates. Before this happens, however, the current source $I_{L S}$ will probably saturate, but clearly we should be able to make $v_{\text {OUT }}$ as negative as $\left(V_{C C}-1\right)$, and achieve $\left|v_{\text {out }}\right|_{\max }=\left(V_{C C}-1\right)$, which is a considerable improvement over the situation in the circuit of Fig.13.14 (see the discussion in the following section).

To "improve" this circuit further, we would want to consider such issues as its dynamic performance, its temperature stability, its manufacturability, etc. First and foremost, however, we would have to know what this circuit was being designed to do. In retrospect this is an obvious consideration, and hopefully you have been concerned by the fact that this issue has not been raised previously in this discussion. It is not our goal to address specific applications in this text, however, and we will leave the issue of further improvements upon this circuit to another text.

Before moving on to a look in the next section at the design of a multistage differential amplifier to meet specific performance objectives, it is interesting to look at a commercial integrated circuit, the 741 operational amplifier. The 741 represented a significant advance in integrated linear amplifier design when it was first introduced and is now recognized as a classic.

The circuit schematic of the 741 is complicated and can be overwhelming unless you first know what to look for in it. Thus, although you can find the full circuit in Fig. 14.5a, it is perhaps best if you first focus your attention on the simplified schematic in Fig. 13.16a. An even better starting point might be the block diagram in Fig. 13.16b, which highlights the basic elements of the circuit. Referring to this figure, we see that the first, or input, stage is an emitter-coupled cascode (see Sec. 13.2.4) biased at a low collector current level to obtain a high input resistance. It has a current mirror load. The second stage is a Darlington common-emitter stage (see Sec. 13.2.3) with a current source load, and the output stage is a push-pull combination (see Sec. 13.2.5).

The 741 circuit is actually very similar to the circuit in Figure 13.15. However, the 741 predates the development of BiCMOS processes that now allow MOSFETs and BJTs to be combined on an integrated circuit chip as we did in Fig. 13.15, so it uses the emitter-coupled cascode instead of a MOSFET for the input stage. The emitter-coupled cascode has excellent high-frequency properties, as we shall study in Chap. 14, and it will have a large input resistance if it is biased at a low level of collector current. To get a low bias level, a Widlar current source, like that shown in Fig. 12.17, is used. (This source is $I_{1}$ in Fig. 13.16a; it is also used to set $I_{2}$ to the proper value.)

The second stage of the 741 differs from that of the circuit in Fig. 13.15 in two important ways. First, it uses a Darlington pair in place of a single transistor to increase the input resistance of this stage and thereby decrease its loading of the first stage. Second, it is based on $n p n$, rather than $p n p$, BJTs. This is done because an $n p n$ is faster than a $p n p$ and in general has higher $\beta$ values. The former feature


FIGURE 13.16
741 operational amplifier: (a) a simplified schematic; (b) a block diagram.
results in a circuit with better high-frequency performance, whereas the latter means that the input resistance will be higher for a given collector bias point.

A final important difference between the 741 and the circuit in Fig. 13.15 is that the 741 does not have a level-shift stage and the quiescent output voltage must be found through other considerations. A little thought will show you that if $I_{3}$ is an ideal current source and $Q_{16}$ and $Q_{17}$ have infinite output resistances $\left(g_{0}=0\right)$, then the voltage on the bases of $Q_{14}$ and $Q_{20}$ can take on a wide range of values just so long as neither $Q_{16}, Q_{17}$, nor the transistors in the current source $I_{3}$ saturate. Since $I_{3}$ is not ideal and it, along with $Q_{16}$ and $Q_{17}$,
has a finite output resistance, the voltage will settle at a value determined by the relative sizes of these output resistances because they essentially form a voltage divider. This is not a very fortunate design result because it is very difficult (probably impossible) to rely on matching output resistances to make a design work; they have too much uncertainty associated with them. So the quiescent value of $v_{\text {OUT }}$ in this circuit is not indeterminate (it will certainly have some value), but it is certainly undesignable.

Actually, the same problem exists in the circuit of Fig. 13.15. As soon as we loaded $Q_{2}$ with a current source we lost control over the voltage on the base of $Q_{3}$.

The solution to this problem lies in the way that high-gain differential amplifiers like the circuits in Fig, 13.15 and 13.16 are used. They are always used in a feedback connection in which some of the output signal is coupled back to the negative input terminal. In this connection the circuit adjusts itself to have a very small quiescent output voltage. That is, a positive voltage results in an input that pushes the output negative, and vice versa. As soon as such a high-gain amplifier is put into such a feedback circuit, its quiescent output settles at zero.

To quantify this discussion, imagine that we have a very high-gain linear amplifier that has a nonzero quiescent output voltage $V_{0}$; that is, the output is $V_{0}$ even though there is zero voltage applied to the input. The input and output voltages of this amplifier will then be related as

$$
\begin{equation*}
v_{\mathrm{OUT}}=A_{\nu} v_{\mathrm{IN}}+V_{0} \tag{13:26}
\end{equation*}
$$

where we assume the voltage gain $A_{\nu}$ is very large and negative. $V_{0}$ is often called the quiescent output offset voltage. This amplifier is illustrated in Fig. 13.17a.

Next consider placing this amplifier in a simple feedback circuit like that in Fig. 13.17b. To show that the magnitude of the output offset voltage is dramatically reduced by doing this, we can calculate $v_{\text {OUT }}$ in this circuit. Summing currents at the input node, we have

$$
\begin{equation*}
\left(v_{S}-v_{\mathrm{IN}}\right) G_{1}-v_{\mathrm{IN}} G_{\mathrm{IN}}+\left(v_{\mathrm{OUT}}-v_{\mathrm{IN}}\right) G_{2}=0 \tag{13.27}
\end{equation*}
$$

(Notice that we write this expression using conductances rather than resistances because it is much more convenient to write node equations this way.) Writing $\dot{\nu}_{\text {IN }}$ as $\left(v_{\text {OUT }}-V_{0}\right) / A_{v}$ and doing a bit of algebraic manipulation, we find

$$
\begin{equation*}
v_{\mathrm{OUT}}=\frac{A_{\nu} G_{1} v_{S}-\left(G_{1}+G_{2}+G_{\mathrm{IN}}\right) V_{0}}{A_{\nu} G_{2}-\left(G_{1}+G_{2}+G_{\mathrm{IN}}\right)} \tag{13.28}
\end{equation*}
$$

If $A_{\nu}$ is very large, the factor $A_{v} G_{2}$ will be dominant in the denominator, and if the input resistance is very large, $G_{\text {IN }}$ will be negligible relative to $G_{1}$ and $G_{2}$. For these conditions the above expression reduces to

$$
\begin{equation*}
v_{\mathrm{OUT}} \approx \frac{G_{1}}{G_{2}} v_{S}-\frac{G_{1}+G_{2}}{G_{2}} \frac{V_{0}}{A_{v}} \tag{13.29a}
\end{equation*}
$$

or, in terms of resistances,

$$
\begin{equation*}
v_{\mathrm{OUT}} \approx \frac{R_{2}}{R_{1}} v_{S}-\frac{R_{1}+R_{2}}{R_{1}} \frac{V_{0}}{A_{\nu}} \tag{13.29b}
\end{equation*}
$$



FIGURE 13.17
High-gain linear amplifier with a nonzero quiescent output offset voltage $V_{0}$ : (a) isolated and without any feedback elements; (b) connected in a simple feedback circuit.

Either way, the first term in this expression should be familiar to you as the gain of this feedback connection. The second term involving $V_{0}$ confirms the reduction in the offset voltage that we argued earlier would occur. The offset is reduced by a factor roughly equal to the ratio of the open-loop voltage gain $A_{y}$ to the feedback stabilized gain $R_{2} / R_{1}$; this ratio can be very large indeed. If, for example, the open-loop voltage gain is greater than 10,000 and the stabilized gain is 20 , the offset is reduced by a factor of over 500 .

As we stated earlier, the actual 741 schematic shown in Fig. 14.5 a looks more complicated than what is shown in Fig. 13.16a. You may now want to look at Fig. $14.15 a$ and identify the basic building-block components shown in Fig. 13.16. (The transistor numbering is the same in these two figures.) Beyond the basic elements, you should also notice the $50-\mathrm{k} \Omega$ resistors added between the bases of $Q_{5}, Q_{6}$, and $Q_{17}$ and ground; these resistors help make the circuit faster by providing a path to discharge the bases of these BJTs.* The exact value of these resistors is not particularly important; they just need to be large. To save space they are actually realized as depletion mode junction field effect transistors with their gate shorted to their source. JFETs made for this purpose are called pinch resistors.

[^18]Note also the 25 - and $50-\Omega$ resistors in the emitter leads of $Q_{17}, Q_{19}, Q_{20}$; these are included to combat thermal runaway (see Sec. 12.5.1c). Finally, notice that an additional provision has been made to adjust the quiescent output voltage with an external resistor attached to the terminals labeled "offset null"; this is used if the scheme described in the preceding paragraph is not satisfactory. Do not be too concerned about the other "extra" elements in the circuit. You may be able to figure out the roles of some of them, but the subtleties of others are well beyond us at this point. The important thing is to see the essential elements.

### 13.4 A DESIGN EXERCISE: A BASIC npn OP-AMP

Perhaps the best way, possibly the only way, to appreciate and truly learn many of the points we have made concerning transistor circuits in the last several chapters is to design an amplifier to meet certain performance specifications. Ideally you will have the opportunity to do this soon in your career. In anticipation of this, and to help you further exercise the analytical skills you have developed in studying this text, we will now consider a design example. Specifically we will consider the choice of resistor values in the operational amplifier (op-amp) circuit illustrated in Fig. 13.14, which has been redrawn in Fig. 13.18a with the full current-source circuits included, to meet the following seven performance goals (unless otherwise specified, all refer to mid-band frequencies):

Differential mode voltage gain: as high as possible
Common mode input voltage swing: as large as possible
Differential mode input resistance: $\geq 10 \mathrm{~K}$ ohms
Output voltage swing into a $1-\mathrm{k} \Omega$ load: approximately 2 V
Differential mode output resistance: $\leq 50 \Omega$.
Quiescent level of output voltage: approximately 0 V
Total quiescent power dissipation: as small as possible
We will assume that all of the transistors are identical, with $\beta_{F}$ equal to 100 for $I_{C Q}$ between 100 nA and 10 mA , and that we must bias the transistors within this range. We will also assume that the resistors must be greater than $50 \Omega$ and less than $15 \mathrm{k} \Omega$, unless we choose to short- or open-circuit them, and that the voltage supplies are +10 V and -10 V .

Furthermore, we will assume for the purposes of this design that the largesignal behavior of the transistors is adequately modeled by a model like that of Fig. $8.19 b$ with $V_{B E, \mathrm{ON}}=0.6 \mathrm{~V}$, and $V_{B C, S A T}=0.4 \mathrm{~V}$; and that the small-signal behavior is suitably modeled by the hybrid- $\pi$ model of Fig. $8.24 a$ with $r_{x}=25 \Omega$ and $g_{o}=I_{C} / V_{A}$, where $V_{A}$ is 50 V .

### 13.4.1 The Parts

To proceed with our design we must first make certain that we understand how each one of the performance goals depends on the circuit parameters (i.e., on

(b)

FIGURE 13.18
(a) Differential amplifier of Fig. 13.14 redrawn with the full current-source circuits shown; (b) the mid-band small-signal linear differential mode equivalent half-circuit model for this amplifier.
the resistor values and transistor bias points). Then we need to look at how the goals are interrelated and at how changing the circuit to improve one performance characteristic affects the circuit's performance in other areas. Finally, we can attempt to find an operating point where all the goals are met. The process can be complex, and successful design usually requires a combination of systematic analysis and intuitive deduction. If you expect all of the answers to come just from equations, the process will take a very long time. So, we will start out fairly systematically, all the while trying to develop insight into the overall problem, so that by the time we must choose the values in our final design we have a good "feel" for the circuit.
a) Differential mode voltage gain $\boldsymbol{A}_{v d}$. To find the differential mode voltage gain $A_{v d}$, we first draw the small-signal half-circuit model for the amplifier, as shown in Fig. 13.18b. The voltage gain of the last two stages will be essentially 1, and the equivalent resistance in parallel with $R_{C 2}$ is very large, so $v_{\text {out }}$ is approximately $-g_{m 2} v_{\pi 2} R_{C 2}$, which gives us

$$
\begin{equation*}
v_{\text {out }} \approx \frac{1}{2} g_{m 2} R_{C 2} g_{m 1} v_{i d} \frac{R_{C 1} r_{\pi 2}}{\left(R_{C 1}+r_{\pi 2}\right)} \tag{13.30}
\end{equation*}
$$

and

$$
\begin{equation*}
A_{\nu d} \approx \frac{1}{2} g_{m 1} R_{C 1} g_{m 2} R_{C 2} \frac{r_{\pi 2}}{\left(R_{C 1}+r_{\pi 2}\right)} \tag{13.31}
\end{equation*}
$$

b) Common mode input voltage swing $\pm v_{I C}$. The inputs can increase in common until $Q_{1}$ saturates and can decrease until $Q_{7}$ sáturates. Thus if we want $v_{I C}$ to be, for example, $\pm 6 \mathrm{~V}$, we must bias $Q_{1}$ so that its collector is at approximately 5.6 V or more. Similarly the reference voltage on the base of $Q_{7}$ must be -6.2 V - that is, $(-6 \mathrm{~V}-0.6 \mathrm{~V}+0.4 \mathrm{~V})$-or less. This value is 3.8 V above the negative supply, so a negative common mode excursion of 6 V would not appear to cause any difficulty in this circuit.

It is important to note that the positive excursion also places a limitation on the gain. In our example of $v_{I C}$ being +6 V , for which the collector of $Q_{1}$ must be at 5.6 V or more above ground, the gain is restricted because the voltage drop across $R_{C 1}$ must correspondingly be 4.4 V (i.e., $V_{C C}-5.6 \mathrm{~V}$ ), or less. Thus we have the constraint that

$$
\begin{equation*}
R_{C 1} I_{C 1} \leq 4.4 \mathrm{~V} \tag{13.32a}
\end{equation*}
$$

or

$$
\begin{equation*}
g_{m} R_{C 1} \leq 4.4 \frac{q}{k T}=176 \tag{13.32b}
\end{equation*}
$$

In arriving at these expressions we have neglected the base current into $Q_{2}$, which also flows through $R_{C 1}$, but this is adequate for the first time through and is standard practice. We will refine things later on.

Before proceeding, remember that the range on $V_{I C}$ is not specified in our design structure but rather is something we want to maximize. We used $\pm 6 \mathrm{~V}$ as an example above simply to have a concrete number to work with.
c) Differential mode input resistance $r_{i d}$. The differential mode input resistance of this circuit is simply $r_{\pi 1}$, which is $\beta k T / q I_{C 1}$. This specification thus places another constraint on $I_{C 1}$, that is,

$$
\begin{equation*}
I_{C 1} \leq \frac{\beta k T}{q r_{i d}} \tag{13.33}
\end{equation*}
$$

Making $r_{i d}$ greater than $10 k$ thus restricts $I_{C 1}$ to 0.25 mA or less.
d) Output voltage swing $\left|v_{o d}\right|_{\text {max }}$. The voltage on the collector of $Q_{2}$ changes directly with $v_{o d}$, so one of the limitations on $\left|v_{o d}\right|_{\max }$ is the allowable swing of this collector voltage. It can increase to 10 V (i.e., $V_{C C}$ ), and it can decrease until $Q_{2}$ saturates, a point determined by the bias on $Q_{1}$. The former consideration constrains the voltage drop across $R_{C 2}$ to be greater than 2 V (i.e., $\left|v_{o d}\right|_{\max }$ ) and thus restricts $g_{m 2} R_{C 2}$ :

$$
\begin{equation*}
g_{m 2} R_{C 2} \geq q\left|v_{o d}\right|_{\max } / k T=80 \tag{13.34}
\end{equation*}
$$

Another possible limitation on the negative excursion of $v_{o d}$ is placed by $R_{E 4}$, as we discussed in Sec. 13.2.5. We must have

$$
\begin{equation*}
-V_{C C} R_{L} /\left(R_{L}+R_{E 4}\right) \leq-\left|v_{o d}\right|_{\max } \tag{13.35}
\end{equation*}
$$

In our case, with $V_{C C}=10 \mathrm{~V}, R_{L}=1 \mathrm{k} \Omega$, and $\left|v_{o d}\right|_{\max }=2 \mathrm{~V}$, we must have $R_{E 4} \leq 4 \mathrm{k} \Omega$.
e) Differential mode output resistance $r_{o d}$. The differential mode output resistance of this circuit can be deduced from the incremental half-circuit in Fig. $13.18 b$ to be given by

$$
\begin{equation*}
r_{o d}=R_{E 4} \| \frac{r_{\pi 4}+R_{E 3}+\left[\left(r_{\pi 3}+R_{C 2}\right) / \beta\right]}{\beta} \tag{13.36}
\end{equation*}
$$

The term $\left(r_{\pi}^{3}+R_{C 2}\right) / \beta^{2}$ is probably very small, so for design purposes our main concerns should be $\left(r_{\pi 4}+R_{E 3}\right) / \beta$ and $R_{E 4}$. We have said that we need $R_{E 4}$ to be less than $4 \mathrm{k} \Omega$, and we will probably make it exactly $4 \mathrm{k} \Omega$ to minimize the quiescent power dissipation. With $R_{E 4}$ so large, the only way we can have $r_{o d}$ less than $50 \Omega$ is if we have $\left(r_{\pi 4}+R_{E 3}\right)$ less than $5 \mathrm{k} \Omega$. Furthermore, if $R_{E 4}$ is $4 \mathrm{k} \Omega$, and VOUT is 0 V , then $I_{C 4}$ will have to be 2.5 mA , which says that $r_{\pi 4}$ is $1 \mathrm{k} \Omega$. Having ( $r_{\pi 4}+R_{E 3}$ ) less than $5 \mathrm{k} \Omega$ and $r_{\pi 4}$ equal to $1 \mathrm{k} \Omega$ means in turn that we must have $R_{E 3}$ less than $4 \mathrm{k} \Omega$. Again, we will want to try to keep $R_{E 3}$ as large as possible to minimize $I_{L S}$ and the quiescent power consumption, so we will probably make it exactly $4 \mathrm{k} \Omega$.
f) Quiescent output voltage $V_{\text {OUT }}$. $V_{\text {OUT }}$ is the voltage level on the collector of $Q_{2}$ less two $0.6-\mathrm{V}$ base-emitter drops and the voltage drop across $R_{E 3}$. Thus, given $R_{E 3}$ and taking into consideration the value of $r_{o d}$, we can adjust $I_{L S}$ to make VOUT zero once we select the bias of $Q_{2}$.
g) Quiescent power dissipation. Summing the quiescent power dissipated in all of the elements to determine the total quiescent power consumption is a hopeless, and fortunately unnecessary, exercise. The efficient way to calculate the power consumption is to focus on calculating the power supplied by the sources, which is simply the sum of the bias currents times the supply voltage. Thus, looking at Fig. 13.18a, we have

$$
\begin{align*}
P= & \left(V_{C C}+V_{E E}\right)\left(I_{C 4}+I_{C 7}+I_{C 8}+I_{C 9}\right) \\
& +V_{E E}\left[I_{C 5}+\frac{1}{\beta}\left(I_{C 5}+I_{C 7}+I_{C 8}+I_{C 9}\right)\right] \tag{13.37}
\end{align*}
$$

The supply voltages are, of course, fixed, so our design latitude lies in reducing the bias currents. We have found restrictions on most of them already but will in general want to keep them small.

### 13.4.2 The Whole

Now that we have had a first look at the factors affecting the individual performance parameters in our circuit, we need to look at how they interact and the compromises we face. There is no right order in which to do this, nor even a best order, so we just have to start someplace and see what happens. We have to be prepared to iterate several times and backtrack when we get into trouble meeting specifications, but hopefully we will eventually be able to focus in on an optimum design.

We will look first at $r_{i d}$ because it is a fairly clean specification. Fixing $r_{i d}$ exactly at $10 \mathrm{k} \Omega$ means that $I_{C 1}$ must be 0.25 mA . We could try to make $r_{i d}$ even :larger, which would reduce the power, but we also know that $I_{C 1}$, or at least the product $I_{C 1} R_{C 1}$, enters into the gain and the common mode voltage swing, so let's wait to see what conclusions these other constraints lead us to.

The next hard constraint is that the amplifier must be able to supply $\pm 2 \mathrm{~V}$ to a $1-\mathrm{k} \Omega$ load. This implies that the collector of $Q_{2}$ must be able to swing at least $\pm 2 \mathrm{~V}$, which says that it must be able to go to as low as 6 V (i.e., $V_{C C}-4 \mathrm{~V}$ ). This in turn says that the base of $Q_{2}$ and thus the collector on $Q_{1}$ must be biased at, at most, 6.4 V above ground, so $I_{C} R_{C 1}$ must be $\geq 3.6 \mathrm{~V}$. Making it larger increases $A_{v d}$ [see Eq. (13.31)], but making it smaller increases $\left|v_{I C}\right|_{\max }$; we clearly have to compromise on these two specifications.

There is yet another factor to consider here. The largest resistor we can have in the circuit is $15 \mathrm{k} \Omega$, so there is in fact an upper bound on $I_{C} R_{C 1}$ since we have $I_{C 1} \leq 0.25 \mathrm{~mA}$ and $R_{C 1} \leq 15 \mathrm{k} \Omega$. In particular, we must have $I_{C 1} R_{C 1} \leq 3.75 \mathrm{~V}$. Fortunately this is not inconsistent with the lower bound of 3.6 V set by $\left|v_{\text {out }}\right|$, but it certainly narrows our options. To proceed, let's assume gain is more important to us and set $I_{C 1} R_{C 1}$ equal to 3.75 V , with $R_{C 1}$ at $15 \mathrm{k} \Omega$ and $I_{C 1}$ at 0.25 mA . Our positive common mode voltage swing will thus be limited to +6.65 V ; call it 6.6 V .

Since we have now set the bias on the collector of $Q_{1}$ at 6.25 V , the collector on $Q_{2}$ can go as low as 5.85 and the voltage drop across $R_{C 2}$, which also enters
$A_{\nu d}$, can be increased from 2 V to 2.15 V . A safer design would use 2.1 V , or perhaps even a bit lower; we will use 2.1 V , and thus the quiescent voltage at the collector of $Q_{2}$ is 7.9 V above ground.

With the bias on $Q_{2}$ set, we can look at making the quiescent output voltage $V_{\text {OUT }}$ zero. Doing so requires a voltage drop of 6.7 V across $R_{E 3}$. If possible we would like to make $R_{E 3}$ as large as possible to minimize $I_{L S}$, so let's try $15 \mathrm{k} \Omega$ for $R_{E 3}$. Thus $I_{L S}$ must be approximately 0.45 mA . $R_{E 3}$ also enters $r_{o d}$, however, so we had best look at this parameter next.

We found an expression for $r_{o d}$ in Eq. (13.36) and argued that we would have to keep ( $r_{\pi 4}+R_{E 3}$ ) below $5 \mathrm{k} \Omega$. Clearly we cannot make $R_{E 3}$ equal to $15 \mathrm{k} \Omega$, but let's see what we can do. We already have a constraint on $r_{\pi 4}$ that was set by $\left|v_{\text {out }}\right|_{\max } . R_{E 4}$ has to be less than $4 \mathrm{k} \Omega$, and thus $I_{C 4}$ will be greater than 2.5 mA , at which bias level $r_{\pi 4}$ is $1 \mathrm{k} \Omega$. This implies, as we have said earlier, that we must have $R_{E 3} \leq 4 \mathrm{k} \Omega$, and fixing $R_{E 3}$ at $4 \mathrm{k} \Omega$ leads to an $I_{L S}$ of 1.7 mA . Notice, however, that increasing $I_{C 4}$ would reduce $r_{\pi 4}$ and allow us to make $R_{E 3}$ larger and $I_{L S}$ smaller. For minimum power, however, we want the sum $I_{L S}+I_{C 4}$ to be a minimum; so it is worth asking whether we gain or lose by increasing $I_{C 4}$ and decreasing $I_{L S}$ in this way, and if we win, what is the optimum situation. Going through this exercise we find that the optimum $I_{C 4}$ is actually less than our current bias point, so it is best to leave $I_{C 4}$ at 2.5 mA .

Looking back, we see that we have actually been able to meet all of the fixed specifications. We can now see how we are doing on the gain, common mode swing, and power. We turn first to the voltage gain since it involves the one thing we don't have yet, the bias current on the second stage. Our expression for $A_{\nu d}$ was given by Eq. (13.31), which we repeat here with $g_{m}$ replaced by $q I_{C} / k T$ :

$$
\begin{equation*}
A_{v d}=\frac{1}{2} \frac{q I_{C 1} R_{C 1}}{k T} \frac{q I_{C 2} R_{C 2}}{k T} \frac{r_{\pi 2}}{\left(R_{C 1}+r_{\pi 2}\right)} \tag{13.38}
\end{equation*}
$$

The first two factors are already set at 150 and 84 , respectively, since the products $I_{C 1} R_{C 1}$ and $I_{C 2} R_{C 2}$ are set at 3.75 V and 2.1 V , respectively. The factor $r_{\pi 2} /$ ( $R_{C 1}+r_{\pi 2}$ ) is still open to design. Looking at it we see that since $R_{C 1}$ is already fixed, this term is maximized by making $r_{\pi 2}$ as large as possible. This we do by minimizing $I_{C 2}$, which, since the product $I_{C 2} R_{C 2}$ is 2.1 V , can be done by picking the maximum value for $R_{C 2}$, or $15 \mathrm{k} \Omega$. Doing this yields $I_{C 2}=0.14 \mathrm{~mA}$, $r_{\pi 2}=18 \mathrm{k} \Omega$, and the factor $r_{\pi 2} /\left(R_{C 1}+r_{\pi 2}\right) \approx 0.55 . A_{v d}$ is thus 3465.

The differential voltage gain is actually somewhat less than this figure because we have made several approximations we might want to reconsider. First, we have ignored the fact that the gain of the last two stages is somewhat less than 1 , but this is a minor correction. Second, and more importantly, we have ignored the base currents, but since $Q_{2}$ is biased at a low level and $Q_{3}$ at a high level, the base current on $Q_{3}$, which flows through $R_{C 2}$, is important. Specifically, if $I_{C 3}\left(\approx I_{L S}\right)$ is $1.7 \mathrm{~mA}, I_{B 3}$ is 0.017 mA . With $R_{C 2}=15 \mathrm{k} \Omega$ and the voltage drop across it being 2.1 V , the current through it, which we have been saying is $I_{C 2}$, is 0.14 mA . Clearly 0.017 mA , or over 10 percent of this current, is $I_{B 3}$, so the portion going
to $Q_{2}$ (i.e., $I_{C 2}$ ) is only 0.123 mA . Thus the product $I_{C 2} R_{C 2}$ is really only about 1.85 V rather than 2.1 V , and $A_{\nu d}$ is thus only 3050.

We should similarly adjust $I_{L S}$ to account for the base current of $Q_{4}$, which is also biased at a large quiescent value. $I_{B 4}$ is 0.025 mA , so $I_{L S}$ should really be 1.675 mA rather than 1.7 mA ; this is not a big deal, perhaps, but it does lead to a difference in the voltage drop across $R_{E 3}$ of 0.1 V .

Next we need to design the current sources, determine the allowable common mode voltage swing, and calculate the power dissipation. The maximum common mode voltage is limited by the voltage on the collector of $Q_{1}$ to +6.6 V , as we said earlier. The minimum common mode voltage is limited by the saturation of $Q_{7}$ and thus depends on the details of the current source design, specifically on the value of the reference voltage $V_{\text {REF }}$ set by $Q_{5}$ on the bases of $Q_{7}, Q_{8}$, and $Q_{9}$; the lower $V_{\text {REF }}$ is, the more negative the common mode voltage can be. Otherwise, this voltage does not affect the amplifier performance significantly; it has only a minor impact on the power dissipation since the base currents of $Q_{7}$, $Q_{8}$, and $Q_{9}$ flow through $R_{C 5}$, and thus we would like to keep the voltage drop across $R_{C 5}$ small. Assuming for the sake of argument that we want a symmetrical common mode voltage swing (i.e., $\pm 6.6 \mathrm{~V}$ ), we can set $V_{\text {REF }}$ at -6.8 V , or 3.2 V above $-V_{E E}$, which is a reasonable value. With this $V_{\text {REF }}$, we can next choose $R_{E 6}, R_{E 7}$, and $R_{E 8}$. Our design values for $I_{C 7}, I_{C 8}$, and $I_{C 9}$ are 0.5 , 0.246 , and 1.7 mA , respectively, so we find that $R_{E 7}$ must be $5.2 \mathrm{k} \Omega, R_{E 8}$ must be $10.6 \mathrm{k} \Omega$, and $R_{E 9}$ must be $1.53 \mathrm{k} \Omega$.

The final parameter we must select is the quiescent collector current in $Q_{5}$. Power considerations would tell us to make this as small as possible by making $R_{C 5}$ equal to $15 \mathrm{k} \Omega$. The corresponding current through $R_{C 5}$ is 0.41 mA (since $V_{\mathrm{REF}}=-6.8 \mathrm{~V}$ ). This is, strictly speaking, not $I_{C 5}$, however, because it also includes the base current to $Q_{6}$. This current equals the sum of the base currents of $Q_{5}, Q_{7}, Q_{8}$, and $Q_{9}$, which turns out to be roughly $40 \mu \mathrm{~A}$, divided by $\beta$. Thus $I_{B 6}$ is only $0.4 \mu \mathrm{~A}$ and can be neglected relative to $I_{C 5}$. Thus $I_{C 5}$ is 0.41 mA , and $R_{E 5}$ must be $6.3 \mathrm{k} \Omega$.

The design is now complete, and we can at last calculate the power dissipation. Summing the power dissipation using Eq. (13.37), we find it is approximately 103 mW , just over 80 percent of which ( 84 mW ) occurs in the output stages, $Q_{3}$ and $Q_{4}$.

### 13.5 BEYOND BASIC: DESIGN WITH BiCMOS

Looking back over our design in the preceding section, it is striking how important the output specifications were. In addition to requiring very high bias levels on the output stages, in this particular design they affected the design all of the way back to the input, where they even limited the maximum common mode voltage. The input resistance specification placed still further constraints on the design. In all of these aspects the improved amplifier design in Fig. 13.15 is far superior to the amplifier we have just analyzed and designed in Sec. 13.4. To help us explore further why this is so, and to see


FIGURE 13.19
Circuit of Fig. 13.15 redrawn with the current-source circuits shown explicitly.
ways of making the improved design even better, the amplifier of Fig. 13.15 is shown again in Fig. 13.19, including the full current-source circuits as well.

An important difference between the amplifier in Fig. 13.18 and that in Fig. 13.19 is that the former uses only passive resistor loads and has only $n p n$ transistors, whereas the latter uses active loads, a larger variety of active device types, and almost no resistors. In fact, it uses both $n p n$ and $p n p$ bipolar transistors and $n$-channel MOSFETs and has only one resistor. Such a circuit is said to use a BiMOS, or BiCMOS, technology.* It is more difficult to fabricate an integrated circuit with so many different transistor types on it, but doing so provides circuit designers with more options and flexibility and lets them extract much higher performance from designs.

You may want to explore the design of the amplifier of Fig.13.19 to meet the same design goals we set in Sec. 13.4 for the amplifier of Fig. 13.18. You will find that the interplay of the stages is now rather different and that a different set of constraints is active, but the same general approach to the design can be used. $\dagger$ We will not do such a complete and detailed design again here; instead we will focus on just one aspect of the circuit's performance, the differential voltage gain.

[^19]The differential mode voltage gain of the first stage of this amplifier is proportional to $g_{m 1}$ times the load resistance, which is the parallel combination of $r_{o 1}$, the output resistance of $Q_{1} ; r_{06}$, the output resistance of $Q_{6}$; and $r_{\pi 2}$, the input resistance of $Q_{2}$. This is in turn simply $g_{m 1}$ divided by the sum of $g_{01}, g_{06}$, and $g_{\pi 2}$. Writing this out, we have

$$
\begin{equation*}
A_{v d 1}=\frac{g_{m 1}}{g_{o 1}+g_{o 6}+g_{\pi 2}} \tag{13.39a}
\end{equation*}
$$

Since $g_{o 1}$ and $g_{o 6}$ are likely to be much smaller than $g_{\pi 2}$, this is essentially $g_{m 1}$ divided by $g_{\pi 2}$ :

$$
\begin{equation*}
A_{v d 1} \approx \frac{g_{m 1}}{g_{\pi 2}} \tag{13.39b}
\end{equation*}
$$

Inserting the bias point dependences of $g_{m 1}$ and $g_{\pi_{2}}$, we then have

$$
\begin{equation*}
A_{v d 1} \approx \sqrt{2 K I_{D 1}} \frac{\beta_{2} k T}{q I_{C 2}} \tag{13.39c}
\end{equation*}
$$

The voltage gain of the second stage is $-g_{m 2}$ times the load resistance seen by this stage, which is somewhat complicated. We have

$$
\begin{equation*}
A_{\nu d 2} \approx-g_{m 2} \cdot r_{o 9}\left\|r_{o 2}\right\|\left\{r_{\pi 3}+\beta_{3}\left[\beta_{4} R_{L}+r_{\pi 4} \|\left(2 r_{d}+r_{\pi 5}\right)\right]\right\} \tag{13.40a}
\end{equation*}
$$

The resistance in parallel with $r_{09}$ and $r_{02}$ will be dominated by the $\beta_{3} \beta_{4} R_{L}$ factor if our transistors have reasonable $\beta$-values and the load resistor $R_{L}$ is not too small; $\beta_{3} \beta_{4} R_{L}$ is in turn likely to be much larger than the parallel combination of $r_{o 9}$ and $r_{o 2}$ (at least, we want this to be the case in our design), so we have

$$
\begin{equation*}
A_{\nu d 2} \approx-g_{m 2}\left(r_{o 9} \| r_{o 2}\right)=-\frac{g_{m 2}}{g_{o 9}+g_{o 2}} \tag{13.40b}
\end{equation*}
$$

which, in terms of the bias point dependences, is

$$
\begin{equation*}
A_{v d 2} \approx-\frac{q\left|V_{A 9} \| V_{A 2}\right|}{k T\left(\left|V_{A 9}\right|+\left|V_{A 2}\right|\right)} \tag{13.40c}
\end{equation*}
$$

It is significant that this gain is solely dependent on device parameters. The only way to increase it is to make the devices better (e.g., to increase $\left|V_{A}\right|$ ).

Combining Eqs. (13.39c) and (13.40c), we find that the total voltage gain of the gain stages is

$$
\begin{equation*}
A_{v d} \approx-\sqrt{2 K I_{D 1}} \frac{\beta_{2}}{I_{C 2}} \frac{\left|V_{A 9}\right|\left|V_{A 2}\right|}{\left(\left|V_{A 9}\right|+\left|V_{A 2}\right|\right)} \tag{13.41}
\end{equation*}
$$

This result tells us that we want to bias the first stage $\left(Q_{1}\right)$ at as large a quiescent drain current as possible. The limit will be set by the common mode input voltage swing and by any power dissipation restrictions. Equation (13.41) also tells us that we want to bias the second stage $\left(Q_{2}\right)$ at as small as possible a level (so that $r_{\pi 2}$ is large); how low we can go will be set by the decrease in $\beta$ at low collector current levels (recall Sec. 8.1.7d). Notice also, however, that as $I_{D 1}$ is increased and $I_{D 2}$ is decreased, the contrast between $r_{\pi 2}$ and $r_{01}$ and $r_{06}$ becomes smaller and the assumption we made to go from Eq. (13.39a) to (13.39b) becomes
weaker. Also, as we make $I_{C 2}$ smaller, $r_{o 2}$ and $r_{o 9}$ increase and it becomes more and more likely that we can no longer assume that $\beta_{3} \beta_{4} R_{L}$ is much larger than the parallel combination of $r_{02}$ and $r_{o 9}$.

The input resistance of $Q_{2}$ clearly plays a major role in limiting the gain of this stage, and it would be nice to be able to reduce the loading that the second stage of this amplifier places on the first. We will look very briefly at two ways we can try to achieve this objective. The first is to replace $Q_{2}$ with a Darlington connection as is done in the 741 (see Fig. 13.16). The second is to replace $Q_{2}$ with a $p$-channel MOSFET; to do this successfully the $p n p$ current mirror must also be replaced with a $p$-MOS current mirror. We will look at these two options in turn in the following two subsections.

### 13.5.1 Darlington Second Stage

Replacing $Q_{2}$ with a Darlington pair, as shown in Fig. 13.20a, significantly increases the input resistance of the second stage, but it can also lead to a nonzero output voltage when there is no input voltage; this so-called null offset problem must be addressed. To see why this is so, consider that, for the original circuit, a circuit designer can balance the first stage by ensuring that the base-emitter voltages on $Q_{6}$ and $Q_{2}$ are identical. This can be done by sizing $Q_{6}$ and $Q_{2}$ so that they have the same quiescent emitter current densities. This means that $V_{B E 6}=V_{B E 2}$, which in turn means that the voltages on the collectors of both transistors $Q_{6}$ are the same (i.e., that the first stage is balanced). In the circuit of Fig. 13.20a, on the other hand, the collector-emitter voltage of the left-hand $Q_{6}$ is $V_{B E 6}$, whereas that of the right-hand $Q_{6}$ is $V_{B E 2^{\prime}}$ plus $V_{B E 2}$, which is roughly 0.6 V higher than the collector-emitter voltage of the right-hand $Q_{6}$. The first stage is clearly no longer balanced, and this imbalance is indistinguishable from an input signal when the amplifier is connected in a feedback circuit like that illustrated in Fig. 13.17. To overcome this problem an additional diode forward voltage drop (i.e., roughly 0.6 V ) must be added in series with the emitter of $Q_{6}$. Three possible ways of doing this are shown in Figs. $13.20 b, c$, and $d$. In Fig. $13.20 b$, diodes (made from transistors) are placed in the emitter leads of each of the two transistors $Q_{6}$. This is a reasonable thing to do, but we can do even better if a second current mirror circuit is used.

One example of using a second current mirror is shown in Fig. 13.20c. In this circuit, a diode is placed in the voltage circuit of the left-hand $Q_{6}$ and its base-emitter voltage is mirrored to the transistor $Q_{6}^{\prime}$ of the right-hand member of the pair. The beauty of this circuit is that the incremental resistance seen when looking in at the collector of the right-hand $Q_{6}$ is now $r_{06}+r_{o 6^{\prime}}$, or twice as much as before. To the extent that this resistance plays a role in limiting the stage gain, this is good; in practice, however, the gain is probably still limited by the input resistance of the Darlington, and this advantage is modest. The problem with this circuit is that yet another base current must be supplied by the left-hand transistor cascode, and this is an imbalance in the circuit that will manifest itself as an offset. We can often live with this imbalance, but it is possible to reduce it significantly using the second current mirror connection șhown in Fig. 13.20d.


FIGURE 13.20
Circuits incorporating a Darlington second stage to reduce the loading between the first and second stages: Simply adding a Darlington as in (a) creates offset problems that can be corrected by adding diodes as in ( $b$ ) or, a better choice, by adding a second current mirror as in (c) and (d). Of these, ( $c$ ) has higher output resistance, but ( $d$ ) is better balanced.

In the circuit of Fig. $13.20 d$ the diode is put in the right-hand leg of the circuit and is mirrored to the left-hand side. We lose the doubling of $r_{06}$ in this design, but we regain most of the balance and symmetry. The only imbalance in currents now lies in the need to supply the base current of $Q_{2}^{\prime}$, which is typically much smaller than that of $Q_{6}$ or $Q_{6}^{\prime}$.*

The final design issue to consider with respect to these circuits concerns sizing the transistors to closely match the values of $V_{B E}$. We have said that they are all roughly 0.6 V , but we can do much better than this-not necessarily with the exact $V_{B E}$ values, but certainly with their differences. If we refer back to the Ebers-Moll model, we see that we have

$$
\begin{equation*}
V_{B E} \approx \frac{k T}{q} \ln \frac{I_{E}}{J_{S E} A_{E}} \tag{13.42}
\end{equation*}
$$

where $A_{E}$ is the emitter-base junction area. Thus if we have two transistors, $Q_{1}$ and $Q_{2}$, biased at different quiescent emitter current levels, $I_{E 1}$ and $I_{E 2}$, then the difference between their base-emitter voltages, $V_{B E 1}$ and $V_{B E 2}$, is simply given by

$$
\begin{equation*}
V_{B E 2}-V_{B E 1}=\frac{k T}{q} \ln \left(\frac{I_{E 2}}{A_{E 2}} \cdot \frac{A_{E 1}}{I_{E 1}}\right) \tag{13.43}
\end{equation*}
$$

This very important result tells us that for every order of magnitude of difference in the emitter current densities in two bipolar transistors, there will be approximately 60 mV difference in their base-emitter voltages. We can use this observation to size the transistors in a circuit to balance values of $V_{B E}$.

### 13.5.2 p-MOS Current Mirror and Second Stage

If we replace the $p n p Q_{2}$ with a MOSFET as shown in Fig. 13.21a, the input resistance of the second stage becomes infinite and the problem of second-stage loading on the first stage is completely eliminated. The first-stage differential mode voltage gain becomes $g_{m 1}$ times the parallel combination of $r_{01}$ and $r_{06}$ :

$$
\begin{equation*}
A_{v d 1} \approx g_{m 1}\left(r_{o 1} \| r_{o 6}\right)=\frac{g_{m 1}}{g_{o 1}+g_{o 6}} \tag{13.44}
\end{equation*}
$$

The expression for the second-stage differential mode voltage gain in terms of the small-signal device model parameters is the same as before, Eq. (13.40b). In terms of the bias point parameters, however, it is quite different because it now depends on the bias point, whereas before [i.e., in Eq. (13.40c)] it did not. To see this we substitute the appropriate expressions into Eq. (13.40b) to obtain

$$
\begin{equation*}
A_{v d 2} \approx-\sqrt{\frac{2 K_{2}}{I_{D 2}}} \frac{\left|V_{A 9}\right|\left|V_{A 2}\right|}{\left|V_{A 9}\right|+\left|V_{A 2}\right|} \tag{13.45}
\end{equation*}
$$

[^20]

FIGURE 13.21
Circuit of Figure 13.19 modified to have a $p$-channel MOSFET second stage: (a) circuit with the $p n p Q_{2}$ simply replaced with a MOSFET; (b) circuit that uses $p$-channel MOSFETs for both $Q_{2}$ and the current mirror.
from which it is clear that we want $K_{2}$ to be as large as possible and $I_{D 2}$ to be as small as practical. How small we can make $I_{D 2}$ depends on two factors. First, as we make $I_{D 2}$ smaller, $r_{o 2}$ and $r_{09}$ increase, and at some point ignoring the other factors in Eq. (13.40a) is no longer possible. Second, reducing $I_{D 2}$ implies reducing ( $V_{G S 2}-V_{T 2}$ ), and, as we discussed in Sec. 11.4.1, there is a practical lower limit on $\left(V_{G S}-V_{T}\right)$ set by subthreshold effects. This limit is typically 3 to $4 k T / q$.

Having made $Q_{2}$ a MOSFET, we should also replace the $p n p$ current mirror with a $p$-channel current mirror, as illustrated in Fig.13.21b. We do this because we want to keep the quiescent voltages at the drains of the two transistors $Q_{6}$ as similar as possible, and this a formidable task if $Q_{2}$ is a MOSFET and the two $Q_{6}$ transistors are BJTs. Even if all of these transistors are MOSFETs as in Fig. $13.21 b$, we still must ensure that $V_{G S 2}$ is equal to $V_{G S 6}$. An easy way to do this is to make $Q_{2}$ and $Q_{6}$ identical except for their gate widths $W$. The gate widths are then designed to be in the same proportion as the quiescent drain currents, that is,

$$
\begin{equation*}
\frac{W_{6}}{W_{2}}=\frac{I_{D 6}}{I_{D 2}} \tag{13.46a}
\end{equation*}
$$

so the drain current densities per unit gate length through the devices are equal; that is,

$$
\begin{equation*}
\frac{I_{D 2}}{W_{2}}=\frac{I_{D 6}}{W_{6}} \tag{13.46b}
\end{equation*}
$$

This ensures that $V_{G S 2}$ and $V_{G S 6}$ are equal.
With regard to the optimum values for $I_{D 2}$ and $I_{D 6}$, we have already seen from Eq. (13.45) that $I_{D 2}$ should be as small as practical. Writing Eq. (13.44a) for $A_{v d 1}$ in terms of the bias point parameters gives us a similar constraint on $I_{D 6}$. We have

$$
\begin{equation*}
A_{v d 1} \approx-\sqrt{\frac{2 K_{1}}{I_{D 1}}} \frac{\left|V_{A 1}\right|\left|V_{A 6}\right|}{\left|V_{A 1}\right|+\left|V_{A 6}\right|} \tag{13.44'}
\end{equation*}
$$

which tells us that $I_{D 1}$, and therefore $I_{D 6}$ (since $I_{D 1}$ and $I_{D 6}$ are identical), should also be as small as practical.

Making $Q_{2}$ a MOSFET and using a $p$-channel current mirror is an excellent design choice, but there are problems with it as well. First, implementing this approach requires being able to fabricate both bipolar and MOS transistors on the same chip (i.e., it requires a BIMOS process). Second, MOSFETs tend to have relatively small Early voltages and relatively low transconductances. Stated more concisely, the $A_{v, \text { max }}$ of MOSFETs is in general low compared to that of BJTs, as we discussed in Sec. 11.4.1b. Having said that, however, we should also point out that the performance differential between pnp BJTs and MOSFETs is often less than between $n p n$ 's and MOSFETs because technologies are often focused on optimizing the performance of $n p n$ 's (possibly at the expense of $p n p$ performance). It is also true that MOSFET performance is continually being improved. The bottom line is that MOS current mirrors are an excellent design choice and are widely used.

### 13.6 SUMMARY

In this chapter we have considered the problem of connecting basic amplifier stages to form multistage amplifiers that have combinations and levels of input and output resistances, as well as gains, not achievable from single stages. We have seen that to combine stages successfully we must pay careful attention to how the stages we are joining interact with regard both to their respective bias conditions and to their small-signal performances. We have studied several approaches that have been developed to address these issues and to simplify the problem of joining, or "cascading," stages.

The simplest way of overcoming the biasing problem is to couple stages with large capacitors that pass the signals through the cascade while keeping the stages isolated for biasing purposes. We call these designs capacitively coupled cascades.

Although convenient conceptually and for discrete designs, the use of capacitors to couple and bias stages is not at all attractive for integrated circuits, where large-value capacitors are difficult to realize. Thus in design for integration, direct coupling without resorting to capacitors is preferred. We have seen that direct coupling of more than two or three gain stages is difficult, however, and that a level-shift stage, as well as output buffer stages, must be added to make a useful direct-coupled amplifier. We have also seen that there are several direct-coupled dual-stage amplifiers that are so useful and important that they can be considered standard building-block stages themselves. In particular, we have introduced the cascode, the Darlington, the emitter-coupled pair, and the push-pull output stage.

We have shown that because of their rejection of common mode input signals, differential pair stages are relatively easy to cascade. And, finally, we have considered at length the analysis and improvement of multistage differential amplifiers and have seen in several specific examples how to design circuits to meet certain performance goals.

## PROBLEMS

13.1 In the bipolar transistor circuit shown in Fig. P13.1 the two $n p n$ transistors are identical and have $\beta_{F}=100$ and $V_{B E, O N}=0.6 \mathrm{~V}$. Calculate the following quantities:
(a) The quiescent collector and base currents in $Q_{1}$ and $Q_{2}$.
(b) The quiescent power dissipation in the circuit. Hint: Sum the currents supplied by the voltage source and multiply by its value (i.e., 6 V ).
(c) The mid-band linear incremental voltage gain $v_{\text {out }} / v_{\text {in }}$.
(d) The mid-band linear incremental input resistance seen at the terminals where $v_{\text {in }}$ is indicated.
(e) The mid-band linear incremental output resistance seen at the terminals where $v_{\text {out }}$ is indicated (i.e., in parallel with the $1-\mathrm{k} \Omega$ load resistance).
13.2 (a) In the amplifier shown in Fig. P13.2a the transistor $Q_{1}$ is used as a diode in a biasing circuit for transistor $Q_{2}$. The two silicon transistors have identical current gain $\beta_{F}$, but the emitter-base area of $Q_{2}$ is twice that of $Q_{1}$. For this circuit we have $\beta_{F}=200$ and $V_{B E, \mathrm{ON}}=0.7 \mathrm{~V}$.


FIGURE P13.1


FIGURE P13.2a


FIGURE P13.2b
(i) Find the approximate dc voltage at the collector of $Q_{2}$.
(ii) Calculate the mid-band voltage gain of this circuit.
(iii) Calculate the mid-band output resistance of this circuit.
(b) The amplifier shown in Fig. P13.2b consists of a common-emitter stage (transistor $Q_{1}$ ) followed by a cascade connection of two emitter-followers $\left(Q_{2}, Q_{3}\right)$, that is, a Darlington connection. The transistors are identical with $\beta=50$ and $V_{B E, O N}=0.7 \mathrm{~V}$.
(i) Find the quiescent currents in each of the load resistors $R_{1}, R_{2}, R_{3}$ shown in the circuit.
(ii) Calculate the mid-band gain of this circuit.
(iii) Calculate the mid-band output resistance of this circuit.
(iv) Calculate the mid-band input resistance of this circuit.
(c) Compare your answers in (iii) of parts a and $b$. The first circuit has commonemitter output stages, whereas the second circuit has two common-collector output stages.
13.3 Consider the emitter-follower/common-base cascade illustrated in Fig. 13.10.
(a) Draw a mid-band linear equivalent circuit for this amplifier using the hybrid- $\pi$ model for $Q_{1}$ and the common-base model (see Fig. $8.25 b$ ) for $Q_{2}$. Assume that both transistors are identical and are identically biased (i.e., $I_{C 1}=I_{C 2}$ ).
(b) Calculate the input resistance seen between the base of $Q_{1}$ and ground. Express your answer in terms of $r_{\pi 1}$ (in the model for $Q_{1}$. and $R_{E}$.
(c) Calculate the mid-band linear small-signal voltage gain $A_{\nu}\left(\equiv v_{\text {out }} / v_{\text {in }}\right)$ of this circuit, paying careful attention to the sign as well as to the magnitude.
(d) Compare and contrast your result in part c:
(i) to a common-emitter amplifier
(ii) to a cascode
(e) Redraw your circuit in part a, adding the intrinsic capacitances (i.e., the $C_{\pi}$ and $C_{\mu}$ terms).
( $f$ ) In the 741 operational amplifier the common-base stage uses a $p n p$ rather than an $n p n$ transistor. What impact would this difference have on
(i) the incremental circuit you drew in part a?
(ii) the input resistance found in part $b$ ?
(iii) the voltage gain found in part $c$ ?
13.4 First consider the circuit in Fig. P13.4a.


FIGURE P13.4a


FIGURE P13.4b
(a) What is the quiescent collector current $I_{C}$ in this circuit?
(b) What is the quiescent value of the output voltage $V_{\text {OUT }}$ ?
(c) What is the incremental voltage gain $A_{v}=v_{\mathrm{out}} / v_{\text {in }}$ of this circuit?

Next consider the circuit in Fig. P13.4b.
(d) Select $R_{1}$ so that the quiescent value of the output voltage is 0 V .
(e) Select $R_{2}$ so that this amplifier can deliver $\pm 3 \mathrm{~mA}$ to a $1-\mathrm{k} \Omega$ load (i.e., so that the output voltage can swing $\pm 3 \mathrm{~V}$.)
(f) Calculate the output resistance of this amplifier (i.e., looking in at the output terminal).
(g) What is the quiescent power dissipation in this amplifier?
13.5 This question concerns the differential amplifier circuit illustrated in Fig. P13.5. All of the transistors in this circuit are identical and may be modeled with $\beta_{F}=$ $100, v_{B E, \mathrm{ON}}=0.6 \mathrm{~V}, v_{C E, S A T}=0.2 \mathrm{~V}$, and $\left|V_{A}\right|=\infty$.
(a) Assume both inputs are grounded. Select $R_{2}$ so that $I_{C}\left(Q_{1}\right)=1 \mathrm{~mA}$.
(b) Assume both inputs are grounded. Select $R_{1}$ so that $V_{\text {OUT }}=0 \mathrm{~V}$.
(c) Assume that a $v_{\text {IN }}$ of 1 V (relative to ground) is applied to Input 1 and that Input 2 is grounded. What are the common and difference mode input voltages?
(d) What is the mid-band linear incremental differential voltage gain of this circuit?
(e) What is the mid-band linear incremental output resistance seen when looking back from the load resistor?
(f) What is the quiescent power dissipation in this circuit?
13.6 This question concerns the circuit illustrated in Fig. P13.6. In this circuit, $Q_{1}$ and $Q_{2}$ are identical transistors with $\beta=200 . V_{B E, O N}=0.6 \mathrm{~V}$ and $V_{C E, S A T}=0.2 \mathrm{~V}$. Three of the resistor values are specified as $R_{1}=1,4 \mathrm{k} \Omega, R_{2}=6 \mathrm{k} \Omega, R_{3}=21$ $\mathrm{k} \Omega$, and $R_{\mathrm{L}}=1 \mathrm{k} \Omega$. The voltage at Point a, relative to ground, is 3 V .
(a) (i) What is the quiescent collector current of transistor $Q_{1}$ ?
(ii) What is $R_{4}$ ?


FIGURE P13.5
(iii) What must $R_{5}$ be to make the quiescent collector current of $Q_{2}$ equal to 2 mA ?
(iv) What is the quiescent power dissipation in this circuit?
(v) What is the input resistance of this amplifier in mid-band?


FIGURE P13.6
(ii) What is the equivalent resistance in series with $C_{3}$, and what is the corresponding breakpoint frequency? Is this a limiting factor at low or high frequency?
(c) (i) What are the maximum allowable voltage swings at point a, (i.e., what is the maximum permissible value of the voltage at point $a$ ), $V_{a, \text { max }}$, and what is the minimum permissible value, $V_{a, \min }$ (both measured relative to ground)?
(ii) What would be the optimum bias voltage for point a, $V_{a Q}$, assuming sinusoidal input voltage signals $v_{\text {in }}$ ? Your answer can be in terms of $V_{a, \text { max }}$ and $V_{a, \text { min }}$ if you wish.
(d) What are the mid-band voltage and current gains of this circuit?

Identify the stages in this circuit, that is, what is the configuration of the $Q_{1}$ stage, and what is it for the $Q_{2}$ stage?
Which transistors are providing a current gain that is greater than 1 , and which are providing a voltage gain that is greater than 1 ?
13.7 The smallest n -MOSFETs in the circuit of Fig. P13.7 have $V_{T}=+1 \mathrm{~V}, \mathrm{~K}=$ $0.5 \mathrm{~mA} / \mathrm{V}^{2}, \eta=0.2$, and $\left|V_{A}\right|=20 \mathrm{~V}$. For the smallest p-MOSFETs, $V_{T}=$ $-1 \mathrm{~V}, \mathrm{~K}=0.2 \mathrm{~mA} / \mathrm{V}^{2}, \eta=0.1$, and $\left|V_{A}\right|=10 \mathrm{~V}$. Both types of transistors must be biased so that $\left|V_{G S}-V_{T}\right| \geq 0.25 \mathrm{~V}$.
(a) Select $R_{1}$ to get the maximum possible differential mode voltage gain at point A.
(b) Calculate the voltage gain of the output stage (i.e., between point A and the output).
(c) Calculate the output resistance of this circuit. Discuss the consequences of having the substrate of the output transistor grounded.


## FIGURE P13.7

(d) Dimension the $p$-MOSFETs in the first and second stages to minimize the output offset voltage.
(e) Calculate the common mode voltage gain of this circuit at point A. Discuss.
$(f)$ Suggest additions to the circuit that might improve its performance.
13.8 Consider the two cascode current mirrors shown in Fig. 13.20c and d.
(a) Calculate and compare the incremental output resistances of each of these designs.
(b) Calculate and compare the output voltage imbalances in the two circuits.
13.9 In the circuit in Fig. P13.9 the npn transistors have $\beta=100$ for $10 \mu \mathrm{~A} \leq I_{C} \leq 10 \mathrm{~mA}$ and $\left|V_{A}\right|=50 \mathrm{~V}$. For the pnp's, $\beta=50$ for $50 \mu A \leq I_{C} \leq 5 \mathrm{~mA}$ and $\left|V_{A}\right|=20 \mathrm{~V}$. For the $p$-channel MOSFETs, $K$ is $0.1 \mathrm{~mA} / \mathrm{V}^{2}, V_{T}$ is $-1 \mathrm{~V},\left|V_{A}\right|$ is 10 V , and the minimum $\left|\nu_{G S}-V_{T}\right|$ is 0.2 V . The resistor $R_{2}$ is $10 \mathrm{k} \Omega$, and in this problem $R_{3}$ is infinite.
(a) To maximize the first-stage gain, should the bias level of $Q_{2}$ be as large or as small as possible, or does it matter?
(b) To maximize the first-stage gain, should the bias level of $Q_{3}$ be as large or as small as possible, or does it matter?
(c) To maximize the second-stage gain, how should the bias level of $Q_{3}$ be set (i.e., large, small, either)?
(d) Specify the quiescent collector currents of $Q_{2}, Q_{3}$, and $Q_{4}$ to get the maximum possible differential mode voltage gain to point A.
(e) What role does the bias level of $Q_{4}$ play in determining the overall amplifier gain?


FIGURE P13.9
(f) (i) What is the output resistance $r_{0}$ of this amplifier as you have designed it in part d?
(ii) What role does the bias level of $Q_{4}$ play in $r_{0}$ ?
(iii) What role does the bias level of $Q_{3}$ play in $r_{0}$, and how would a design constraint on $r_{o}$ have changed your answer in part d ?
13.10 Consider the circuit of Problem 13.9 when $R_{3}$ is $50 \mathrm{k} \Omega$.
(a) What effect does this change have on the first-stage gain if you leave the bias level of $Q_{3}$ the same as in your design in Problem 13.9?
(b) Can the bias level of $Q_{3}$ be changed to increase the first-stage gain, and what effect will such a change have on the second-stage gain?
(c) What effect does changing the bias level of $Q_{3}$ have on the output resistance of this amplifier?
13.11 This problem concerns the imbalance in the first stage of the circuit in problem 13.9 caused by the Darlington load. (If you did not work problem 13.9, work this problem assuming $I_{C 2}$ is 0.1 mA and $I_{C 3}$ is 1 mA .)
(a) Assuming all of the $n p n$ 's are identical-size devices, what is the difference in the voltages at the collectors of $Q_{8}$ and $Q_{9}$ ?
(b) Suppose that you can make some of the transistors in this circuit larger. The gate widths can be made as much as 10 times wider, and the emitter-base areas can be made up to 20 times larger. The current operating ranges of the devices scale in direct proportion to these changes. Can you use this design freedom to reduce the voltage difference in part a ? (Maintain the same bias levels.)
Consider next modifying the circuit by using a cascode current mirror like that in Fig. 13.20d.
(c) What is the voltage difference between the collectors of $Q_{8}$ and $Q_{9}$ now, assuming all devices are identical?
(d) Can you scale the devices now and reduce this voltage difference, and if you can, what should be done?
(e) What impact does making $R_{3}$ equal to $50 \mathrm{k} \Omega$ have on your answers in parts c and d ?
(f) What is the common mode input voltage range of this circuit with and without the cascode current mirror?
13.12 (a) Redesign the output stage of the circuit of Problem 13.9 using a complementary pair stage like that in Fig. 13.13b.
(b) Derive an expression for the output resistance of your new design.
(c) Compare the quiescent power dissipation levels in the old and new designs of this amplifier. (If you did not work Problem13.9, do this assuming $I_{C 2}$ is $0.1 \mathrm{~mA}, I_{C 3}$ is 1 mA , and $Q_{4}$ is 1 mA .)

## CHAPTER 14

## HIGH-FREQUENCY ANALYSIS OF LINEAR AMPLIFIERS

Now that we have studied the biasing and mid-band analysis of various linear amplifier configurations and are starting to understand some of the issues of amplifier design, we will turn in this chapter to considerations of amplifier operation at high frequencies. One of the general problems facing device, circuit, and system designers is how to get ever-higher performance at ever-higher frequencies from their designs. In preparation for doing this ourselves, we will consider here several aspects of high-frequency analysis of linear amplifiers. First, we consider techniques for determining the bounds of the mid-band frequency range for an arbitrary amplifier design. Then we look at the high-frequency behavior of some specific building-block circuits in an attempt to gain insight into how we should expect various common amplifier configurations to perform. Finally, we conclude by looking at figures of merit through which the inherent, intrinsic high-frequency potential of devices can be evaluated independent of any additional constraints placed upon them by the circuits in which they are being used.

### 14.1 DETERMINING THE BOUNDS OF THE MID-BAND RANGE

In Sec. 11.2 we introduced the concept of the mid-band frequency range of an amplifier; we said that the mid-band range was bounded on the low-frequency side by a limit we called $\omega_{\mathrm{LO}}$ and on the high side by $\omega_{\mathrm{HI}}$. Below $\omega_{\mathrm{LO}}$, the various capacitors we have added to the circuit for coupling stages and for bypassing
resistors are no longer effectively short circuits. The gain is smaller at frequencies below $\omega_{\mathrm{LO}}$ than it is in the mid-band range. Above $\omega_{\mathrm{HI}}$, the capacitors intrinsic to the transistors themselves begin to shunt significant amounts of signal current around the active region of the device and the gain is again lower than it is in the mid-band range. Our task now is to determine what $\omega_{\mathrm{LO}}$ and $\omega_{\mathrm{HI}}$ are for a given circuit.

The methods we will describe, the methods of open- and short-circuit time constants, are based on rigorous linear circuit analyses that we will not attempt to duplicate here and that we only mention by way of providing assurance that these methods are well-founded theoretically. They are approximations, as we shall point out as we go along, and give only approximate bounds. Thus, like much we have learned, they require modeling skill to implement efficiently.

We begin by considering $\omega_{\mathrm{HI}}$. We then do an example and briefly look at $\omega_{\mathrm{LO}}$.

### 14.1.1 Method of Open-Circuit Time

## Constants

To determine $\omega_{\mathrm{HI}}$, we need to know at what frequency one or more of the various intrinsic capacitors $-C_{\pi}$ and $C_{\mu}$ in the case of a bipolar transistor, $C_{g d}$ and $C_{g s}$ in the case of an FET-start to shunt appreciable current past the resistors in parallel with them. It can be shown that we can obtain a conservative estimate for $\omega_{\mathrm{HI}}$ by looking at each of the intrinsic capacitors individually, calculating the resistance in parallel with them under the assumption that all of the other intrinsic capacitors are still perfect open circuits, and then taking $\omega_{\mathrm{HI}}$ as a weighted sum of the various $R C$ products thus calculated.

Specifically, the procedure for this method is as follows:

1. Pick one intrinsic capacitor, call it $C_{i}$, and assume all of the others are perfect open circuits.
2. Determine the resistance, call it $R_{i}$, in parallel with $C_{i}$ with all of the independent sources set equal to zero and with all of the other intrinsic capacitors treated as open circuits.
3. Calculate $\omega_{i}$, defined as $\left(R_{i} C_{i}\right)^{-1}$.
4. Repeat steps 1 through 3 for all of the intrinsic capacitors.
5. When $\omega_{i}$ has been calculated for all of the relevant capacitors, calculate $\omega_{\mathrm{HI}}^{*}$, which is defined as follows:

$$
\begin{equation*}
\omega_{\mathrm{HI}}^{*} \equiv\left[\sum_{i}\left(\omega_{i}\right)^{-1}\right]^{-1} \tag{14.1a}
\end{equation*}
$$

which is also

$$
\begin{equation*}
\omega_{\mathrm{HI}}^{*} \equiv\left[\sum_{i} R_{i} C_{i}\right]^{-1} \tag{14.1b}
\end{equation*}
$$

Linear circuit analysis tells us that the actual mid-band high-frequency breakpoint $\omega_{\mathrm{HI}}$ of the amplifier in question will always be greater than or equal to $\omega_{\mathrm{HI}}^{*}$. That is,

$$
\begin{equation*}
\omega_{\mathrm{HI}} \geq \omega_{\mathrm{HI}}^{*} \tag{14.2}
\end{equation*}
$$

This technique of estimating $\omega_{\mathrm{HI}}$ is called the method of open-circuit time constants.

Notice that summing the individual breakpoint frequencies as in Eq. (14.1) gives the most weight to the $\omega_{i}$ with the smallest values. It also results in an $\omega_{\mathrm{HI}}^{*}$ that is lower than any of the individual $\omega_{i}$.

## Example

Question. Consider an amplifier containing six capacitors limiting high-frequency performance. The open-circuit breakpoint frequencies $\omega_{i}$ corresponding to these six capacitors are $1,5,10,30,50$, and 100 MHz . Estimate $\omega_{\mathrm{HI}}$ for this circuit.

Discussion. Applying Eq. (14.1a), we calculate that $\omega_{\mathrm{HI}}^{*}$ is $(1 / 1+1 / 5+1 / 10+$ $1 / 30+1 / 50+1 / 100)^{-1}=(1.363)^{-1}=0.73 \mathrm{MHz}$. Clearly the lowest opencircuit breakpoint frequency, 1 MHz , dominates this result, and the poles at 5 and 10 MHz also play important roles, together reducing $\omega_{\mathrm{HI}}^{*}$ to 0.77 MHz . The final three poles only decrease $\omega_{\mathrm{HI}}^{*}$ roughly $5 \%$ more.

Interestingly, it can be shown that $\omega_{\mathrm{HI}}$, the true breakpoint frequency, can always be written as a sum like that in Eq. (14.1). Our method of estimating $\omega_{\mathrm{HI}}$ based on Eq. (14.1) is approximate, however, because the procedure used to calculate the individual $\omega_{i}$ terms is approximate. A little thought shows that this fact is not surprising since clearly not all of the other capacitors are open circuits at the breakpoints of many of the capacitors, especially those for which $\omega_{i}$ is much greater than $\omega_{\mathrm{HI}}^{*}$. You could consider improving on the method outlined above by modifying the procedure of calculating $\omega_{\mathrm{HI}}^{*}$ by, for example, recalculating all of the $\omega_{i}$ except the smallest and starting with the second smallest by assuming that all of the capacitors yielding smaller $\omega_{i}$ values are short circuits. This sort of refinement is seldom called for, however. The fact that the present method gives a conservative (i.e., low) bound for $\omega_{\mathrm{HI}}$ means it provides a safe "quick and dirty" estimate that is usually adequate. If a more precise number is required, it would be more reasonable to do a computer analysis using any of a number of available simulation programs.

### 14.1.2 Method of Short-Circuit Time Constants

There is a technique analogous to that used in the preceding subsection to find $\omega_{\mathrm{HI}}^{*}$ that can be used to estimate the low-frequency breakpoint $\omega_{\mathrm{LO}}$ of the midband gain of an amplifier. This technique, called the method of short-circuit time
constants, focuses on the extrinsic capacitors used to couple inputs, outputs, and adjacent stages and to shunt biasing resistors. It proceeds as follows:

1. Pick one extrinsic capacitor, call it $C_{j}$, and assume all of the others are perfect short circuits.
2. Determine the resistance, call it $R_{j}$, in parallel with $C_{j}$ with all of the independent sources set equal to zero and with all of the other extrinsic capacitors treated as short circuits.
3. Calculate $\omega_{j}$, defined as $\left(R_{j} C_{j}\right)^{-1}$.
4. Repeat steps 1 through 3 for all of the intrinsic capacitors.
5. When $\omega_{j}$ has been calculated for all of the relevant capacitors, calculate $\omega_{\text {LO }}^{*}$, which is defined as follows:

$$
\begin{equation*}
\omega_{\mathrm{LO}}^{*} \equiv \sum_{J} \omega_{j} \tag{14.3a}
\end{equation*}
$$

which is also

$$
\begin{equation*}
\omega_{\mathrm{LO}}^{*} \equiv\left[\sum_{J}\left(R_{j} C_{j}\right)^{-1}\right] \tag{14.3b}
\end{equation*}
$$

The actual mid-band frequency breakpoint $\omega_{\text {LO }}$ of the amplifier in question will always be less than or equal to $\omega_{\mathrm{LO}}^{*}$. That is,

$$
\omega_{\mathrm{LO}} \leq \omega_{\mathrm{LO}}^{*}
$$

Note that this time the sum of the individual breakpoint frequencies in Eq. (14.3) favors the largest of the $\omega_{j}$ and results in an $\omega_{\mathrm{LO}}^{*}$ that is larger than any of the individual $\omega_{j}$ terms. The same comments can be made here as were made in the discussion of $\omega_{\mathrm{HI}}$ with respect to the accuracy of this technique. Suffice it to say that it is a very useful back-of-the-envelope method for estimating $\omega_{\text {LO }}$.

### 14.2 EXAMINATION OF SPECIFIC CIRCUIT TOPOLOGIES

The methods outlined in Sec. 14.1 are useful for quantifying the mid-band range. But it is also important that as a circuit designer, you have an intuitive feel for which capacitors will limit the high-frequency performance of a circuit. To this end we will now look at several of our standard building-block stages to develop some general rules of thumb that can guide our consideration of more complicated circuits.

### 14.2.1 Common-Emitter/Source

The first circuit we will consider is the common-emitter amplifier shown in Fig. 14.1a. The small-signal linear equivalent circuit for this amplifier including the intrinsic parasitic capacitances $\mathrm{C}_{\pi}$ and $\mathrm{C}_{\mu}$, is presented in Fig. 14.1b. Notice


FIGURE 14.1
(a) Common-emitter amplifier like that first introduced in Sec. 11.3.1;
(b) the small-signal linear equivalent circuit, including the instrinsic parasitic capacitances $C_{\pi}$ and $C_{\mu}$.
that in the equivalent circuit we have introduced several new elements that are defined as follows:

$$
\begin{gather*}
R_{S} \equiv R_{B 1}\left\|R_{B 2}\right\| R_{T}  \tag{14.4a}\\
R_{L}^{\prime} \equiv R_{L}\left\|R_{C}\right\| r_{o}  \tag{14.4b}\\
v_{S} \equiv v_{T} \frac{\left(R_{B 1} \| R_{B 2}\right)}{\left(R_{T}+R_{B 1} \| R_{B 2}\right)} \tag{14.4c}
\end{gather*}
$$

Notice also that we include the base resistance $r_{x}$ in the incremental model because it may be comparable to $R_{S}$; the size of $r_{x}$ relative to $R_{S}$ is what is important in determining the breakpoint frequency. Previously, in determining voltage gain, it was the size of $r_{x}$ relative to $r_{\pi}$ that was important. We will write the sum of $R_{S}$ and $r_{x}$ as $R_{S}^{\prime}$.

Assuming a small-signal sinusoidal input signal, we can calculate the complex voltage gain $A_{\nu}(j \omega) \equiv v_{\text {out }}(j \omega) / v_{s}(j \omega)$. Doing so we obtain

$$
\begin{equation*}
A_{\nu}(j \omega)=-\frac{G_{s}^{\prime}\left(g_{m}-j \omega C_{\mu}\right)}{(j \omega)^{2} C_{\pi} C_{\mu}+j \omega\left[G_{L}^{\prime} C_{\pi}+\left(G_{L}^{\prime}+G_{S}^{\prime}+g_{\pi}+g_{m}\right) C_{\mu}\right]+G_{L}^{\prime}\left(g_{\pi}+G_{S}^{\prime}\right)} \tag{14.5}
\end{equation*}
$$

where $G_{S}^{\prime}$ is defined as $1 / R_{S}^{\prime}$, or $1 /\left(R_{S}+r_{x}\right)$. A bit of algebra and some consideration of the relative sizes of several terms in the denominator shows us that the roots of the denominator can be approximated as*

$$
\begin{gather*}
\omega_{1} \approx \frac{\left(g_{\pi}+G_{S}^{\prime}\right)}{\left[C_{\pi}+\left(G_{L}^{\prime}+G_{S}^{\prime}+g_{\pi}+g_{m}\right) R_{L}^{\prime} C_{\mu}\right]}  \tag{14.6a}\\
\omega_{2} \approx \frac{G_{L}^{\prime}}{C_{\mu}}+\frac{\left(G_{L}^{\prime}+G_{S}^{\prime}+g_{\pi}+g_{m}\right)}{C_{\pi}} \tag{14.6b}
\end{gather*}
$$

The root of the numerator is

$$
\begin{equation*}
\omega_{3}=\frac{g_{m}}{C_{\mu}} \tag{14.6c}
\end{equation*}
$$

We can also show that of these three frequencies, $\omega_{1}$ is clearly the smallest. $\dagger$ Thus we can interpret $\omega_{1}$ as the upper limit of the mid-band range, $\omega_{\mathrm{H}}$. Much below $\omega_{1}, A_{v}(j \omega)$ is real and has its mid-band value

$$
\begin{equation*}
A_{v}(\text { mid-band })=-g_{m} R_{L}^{\prime} \frac{G_{S}^{\prime}}{\left(g_{\pi}+G_{S}^{\prime}\right)} \tag{14.7}
\end{equation*}
$$

At $\omega=\omega_{1}, A_{\nu}(j \omega)$ has a phase of $45^{\circ}$ and its magnitude is 0.707 of its mid-band value; for $\omega>\omega_{1},\left|A_{\nu}(j \omega)\right|$ decreases as $1 / \omega$.

This is all fine, but it is just a lot of mathematics. You probably aren't getting much general insight from the discussion thus far. To correct this situation we need to look first at our expression for $\omega_{1}$, Eq. (14.6a), and then at our circuit, Fig. $14.1 b$.

Looking at our expression for $\omega_{1}$, we see that $\omega_{1}$ is the characteristic frequency of the parallel combination of two conductances, $g_{\pi}$ and $G_{S}^{\prime}$, and two capacitors, $C_{\pi}$ and $C_{\mu}^{\prime}$, where we define $C_{\mu}^{\prime}$ as $\left(G_{L}^{\prime}+G_{S}^{\prime}+g_{\pi}+g_{m}\right) R_{L}^{\prime} \cdot C_{\mu}$. If $g_{m}$ is much greater than $G_{S}^{\prime}$, as it typically is, ${ }^{\ddagger}$ and since $g_{m}$ is $\beta_{F}$ times larger

[^21]than $g_{\pi}$, then the factor multiplying $C_{\mu}$ is approximately ( $1+g_{m} R_{L}^{\prime}$ ). Recognizing $g_{m} R_{L}^{\prime}$ as the magnitude of the mid-band voltage gain of the transistor, $v_{\text {out }} / \nu_{\pi}$, we understand that this is a large factor and that $C_{\mu}$ somehow now looks much larger in terms of its effect on the circuit breakpoint than it physically is. Since a larger capacitor implies a lower breakpoint frequency, this is a significant (often detrimental) effect. We will explore this further in Sec. 14.2.2 after we look at the common-source stage next.

The situation with the common-source stage is very similar to that with the common-emitter. The small-signal linear equivalent circuit for a common-source stage like that in Fig. 11.11c on page 347, including the parasitic capacitances $C_{g s}$ and $C_{g d}$, is shown in Fig. 14.2. We have not included the source-to-substrate or drain-to-substrate capacitances since they are small and are an unnecessary complication at this point in our investigation.

The topology in Fig. 14.2 is identical to the common-emitter equivalent circuit in Fig. $14.1 b$ with $r_{\pi}$ infinite and $r_{x}$ zero. These are two rather important differences, as we shall see. The latter says that the $R_{S}^{\prime}$ we had earlier (here it is just $R_{T}$ ) can now actually be zero (it could only be as small as $r_{x}$ in a BJT circuit), and the former leads to problems when $R_{T}$ is very large (i.e., with a current source drive).

To find the time constants we calculate the small-signal complex voltage gain for sinusoidal input and get an expression analogous to Eq. (14.5). We find

$$
\begin{equation*}
A_{v}(j \omega)=-\frac{G_{T}\left(g_{m}-j \omega C_{g d}\right)}{(j \omega)^{2} C_{g s} C_{g d}+j \omega\left[G_{L}^{\prime} C_{g s}+\left(G_{L}^{\prime}+G_{T}+g_{m}\right) C_{g d}\right]+G_{L} G_{T}} \tag{14.8}
\end{equation*}
$$

We solve for the roots in the same way we did in the case of Eq.(14.5) and find that the roots of the denominator are

$$
\begin{align*}
& \omega_{1} \approx \frac{G_{T}}{C_{g s}+\left[1+\left(G_{T}+g_{m}\right) R_{L}^{\prime}\right] C_{g d}}  \tag{14.9a}\\
& \omega_{2} \approx \frac{G_{L}^{\prime}}{C_{g d}}+\frac{\left(G_{L}^{\prime}+G_{T}+g_{m}\right)}{C_{g s}} \tag{14.9b}
\end{align*}
$$



FIGURE 14.2
Incremental equivalent circuit for the common-source amplifier of Fig. $11.11 c$, including $C_{g s}$ and $C_{g d}$.

The root of the numerator is

$$
\begin{equation*}
\omega_{3}=\frac{g_{m}}{C_{g d}} \tag{14.9c}
\end{equation*}
$$

The lowest frequency is again $\omega_{1}$, which is effectively $\omega_{\mathrm{H}}$ for the common-source stage. Looking at Eq. (14.9a), the first thing to notice is that the capacitor bridging the input and output, $C_{g d}$ in this circuit, again appears multiplied by a large factor, $\left(G_{T}+g_{m}\right) R_{L}^{\prime}$. $G_{T}$ will often be smaller than $g_{m}$, so the factor $\left(G_{T}+g_{m}\right) R_{L}^{\prime}$ is approximately $g_{m} R_{L}^{\prime}$, which is again the magnitude of the mid-band voltage gain just as it was in the common-emitter stage. We will discuss this phenomenon extensively in Sec. 14.2.2.

The signal-source resistance $R_{T}$ plays an important role in this stage. Notice that for very large $R_{T}$ (or small $G_{T}$ ), which corresponds most nearly to a current source input, we find that $\omega_{1}\left(\approx \omega_{\mathrm{HI}}\right)$ is very small and that the mid-band range is pushed to very low frequencies. This is, consequently, not an attractive input situation if a frequency-independent response is sought. (See Sec. 14.3.2 for further discussion.)

Notice, finally, that if $G_{T}$ is very large and the input approximates an ideal voltage source, then $\omega_{1}$ approaches $1 / R_{L}^{\prime} C_{g d}$. This drive condition yields the largest $\omega_{\mathrm{HI}}$ and widest mid-band region.

In all cases, $C_{g d}$ plays an important role in setting $\omega_{\mathrm{H}}$. It is thus worth realizing that $C_{g d}$ can be zero in an ideal MOSFET and in reality can be made very small using a self-aligned gate technology, as described at the end of Sec. 10.1. This is in contrast to the situation in a BJT, where $C_{\mu}$ is unavoidable because the base-collector junction is an intrinsic part of a bipolar transistor. In general for a MOSFET, $C_{g s}$ is much larger than $C_{g d}$. Whether $C_{g s}$ or $C_{g d}$ dominates $\omega_{1}$ [see Eq. (14.9a)], however, depends on the size of $C_{g d}$ relative to $C_{g s}$ and on the size of the Miller effect (see next section).

### 14.2.2 The Miller Effect

The magnification of $C_{\mu}$ and $C_{g d}$ that we have seen in the common-emitter and common-source circuits is called the Miller effect and was first described for vacuum tube circuits. It is easiest to understand by looking at one of the circuits, say the common-emitter stage in Fig. $14.1 b$, and focusing on the voltage across the capacitor that couples the input and output (i.e., $C_{\mu}$ in the common-emitter). The voltage relative to ground on the left-hand terminal of $C_{\mu}$ is $v_{\pi}$; the voltage on the right-hand terminal relative to ground is $v_{\text {out }}$, which is approximately $-g_{m} R_{L}^{\prime} v_{\pi}$. We must say "approximately" because this is the mid-band expression and it ignores the fact that there might be current flowing through $C_{\mu}$. Nonetheless, if we say that $v_{\text {out }}$ is approximately $-g_{m} R_{L}^{\prime} v_{\pi}$, we see that the voltage across $C_{\mu}$ is $\left(1+g_{m} R_{L}^{\prime} \nu_{\pi}\right)$ and that the current into it from the left is $j \omega C_{\mu}\left(1+g_{m} R_{L}^{\prime}\right) v_{\pi}$. Thus, looking into $C_{\mu}$ from the left, it appears to be a much larger capacitor than it really is. It looks like a capacitor $C_{\mu}^{*}$ whose value is $\left(1+g_{m} R_{L}^{\prime}\right) C_{\mu}$.

The above discussion can be generalized to any capacitor that sits astride a stage with gain; Fig. 14.3 illustrates this point. In Fig. $14.3 a$, a capacitor $C_{M}$

(a)

(b)

(c)

FIGURE 14.3
(a) Amplifier stage with a capacitor $C_{M}$ bridging the input and output terminals; (b) the circuit of (a) with the bridging capacitor replaced by the equivalent capacitances seen from the left and from the right; (c) the incremental equivalent circuit for the common-emitter amplifier of Fig. $14.1 b$ after it has been simplified by taking the Miller effect into account.
is shown bridging the input and output terminals of a stage with a voltage gain $A_{\nu}$. The voltage across the capacitor is clearly $\nu_{1}\left(1-A_{\nu}\right)$, so from the left it looks like a capacitor of magnitude $\left(1-A_{\nu}\right) C_{M}$, as illustrated in Fig. 14.3b. From the right it looks essentially unchanged, as Fig. $14.3 b$ also illustrates.

In addition to vividly illustrating the implications of the Miller effect, the circuit in Fig. $14.3 b$ is much easier to analyze than the circuit of Fig. 14.3a because it separates naturally into easily analyzed segments. With $C_{M}$ bridging the input and output as in Fig. 14.3a, the circuit has to be analyzed as a whole and the exercise quickly becomes counterproductive.

The equivalent circuit in Fig. 14.1b has been modified in Fig. 14.3c using the Miller effect result. The voltage gain has been taken to be $-g_{m} R_{L}^{\prime}$, which is its mid-band value. If we apply the open-circuit time constant technique to this circuit we find two frequencies:

$$
\begin{gather*}
\omega_{a}=\frac{\left(g_{\pi}+G_{S}^{\prime}\right)}{\left[C_{\pi}+\left(1+g_{m} R_{L}^{\prime}\right) C_{\mu}\right]}  \tag{14.10a}\\
\omega_{b}=\frac{1}{R_{L}^{\prime} C_{\mu}} \tag{14.10b}
\end{gather*}
$$

Clearly, $\omega_{a}$ is much less than $\omega_{b}$, so $\omega_{\mathrm{HI}}^{*}$ is essentially $\omega_{a}$.
It is now interesting (and important) to compare this result with our earlier estimate of $\omega_{\mathrm{HI}}$, namely $\omega_{1}$ in Eq. (14.6a). Doing this we see that the two expressions are nearly identical. They differ only in the denominator where Eq. (14.6a) has the sum ( $G_{S}^{\prime}+g_{\pi}+g_{m}$ ) in place of simply $g_{m}$. However, we know that $g_{m}$ is $\beta_{F}$ times larger than $g_{\pi}$, so clearly $g_{\pi}$ can be neglected relative to $g_{m}$. Furthermore, the factor $G_{S}^{\prime}$ is typically much smaller than $g_{m}$. In such cases our two estimates of $\omega_{\mathrm{HI}}$ [i.e., Eqs. (14.6a) and (14.10a)], are equivalent and we can say

$$
\begin{equation*}
\omega_{\mathrm{HI}}(\text { common-emitter }) \approx \frac{\left(g_{\pi}+G_{S}^{\prime}\right)}{\left(C_{\pi}+g_{m} R_{L}^{\prime} C_{\mu}\right)} \tag{14.11}
\end{equation*}
$$

As an aside before summarizing our discussion, notice that we have not tried to compare the other breakpoint frequency we found using the Miller approximation and the open-circuit time constant method (i.e., $\omega_{b}$ ) with $\omega_{1}$ in Eq. (14.6b) because the open-circuit time constant method is not valid for such a comparison. Its purpose is only to estimate the lowest breakpoint frequency; it is not a valid way to calculate any of the other breakpoint frequencies.

To summarize, we have learned that a capacitor in the Miller position (i.e., bridging the input and output of an amplifier with a large negative voltage gain $A_{v}$ ) has a detrimental impact on the high-frequency response of the circuit far greater than we would normally expect based on its value alone. In the Miller position the capacitor's apparent size is approximately $\left|A_{\nu}\right|$ times greater. This effect, which is important because this can so significantly reduce the $\omega_{\mathrm{HI}}$ of an amplifier, is particularly important in high-gain common-emitter and commonsource amplifiers.

Normally the Miller capacitor effect is viewed as a problem because it reduces $\omega_{\mathrm{HI}}$; it is thus something to be avoided. There are some situations, however, in which a large capacitor is actually needed in a circuit and where the Miller effect can be used to advantage. An interesting example is found in the 741 operational amplifier integrated circuit. In the 741 circuit, the parasitic bipolar transistor capacitors (i.e., the $C_{\pi}$ and $C_{\mu}$ capacitors) create relatively closely spaced highfrequency poles; the situation is illustrated by the dashed curves in Figs. 14.4a and $b$. Above $\omega_{\mathrm{HI}}$ the magnitude of the gain decreases and additional phase shift $\left(90^{\circ}\right)$ is introduced by each pole. If the magnitude of the gain is still greater than 1 well above the second pole, where the phase shift is $180^{\circ}$ or more, as it is in the situation illustrated by the dashed curves in Fig. 14.4, there can be positive feedback between the output and the input and the circuit can oscillate, which is not a good situation. Operational amplifiers like the 741 are especially susceptible to this problem because they have such large low-frequency gains. The magnitude


FIGURE 14.4
Bode plots of the voltage gain of a typical operational amplifier without (dashed curves) and with (solid curves) compensation: (a) the magnitude; (b) the phase.
of the gain has to decrease a great deal before it is less than 1 , and if the poles are closely spaced a large amount of phase shift can be introduced while the gain is still high (see Fig. 14.4).

To solve this problem a lower-frequency pole is intentionally introduced by adding a capacitor, called a compensating capacitor, to the circuit. The pole $\omega_{c}$ is made far enough below the next higher pole that by the time the higher pole is reached the gain will be less than 1, as the solid curves in Fig. 14.4 illustrate. Of course, $\omega_{\mathrm{HI}}$ is reduced significantly by adding a compensating capacitor, but this is the price that must be paid to eliminate the possibility of oscillation and to thereby obtain a useful, stable high-gain amplifier.

In many early integrated-circuit operational amplifiers, leads were provided so that a separate discrete compensating capacitor could be added externally to the circuit because it was hard to make a large enough capacitor on the integrated circuit itself. In the 741, the capacitor is actually made on the integrated circuit; the problem of making it large enough is solved by placing it in a Miller position. This is illustrated in Fig. 14.5a, which shows the 741 schematic; the capacitor in question is $C_{1}$, and it bridges transistor $Q_{16}$. Using this trick, the actual capacitance needed is only 30 pF , as opposed to the several nanofarads that would be needed otherwise. Even then, however, this much smaller capacitor still takes almost $10 \%$ of the chip area and is much larger than any of the resistors or transistors in the circuit, as the photomicrograph in Fig. 14.5 b clearly illustrates.

### 14.2.3 Degenerate-Emitter/Source

Adding degeneracy to a common-emitter or common-source stage changes the Miller effect only in that since the voltage gain of this stage is smaller, so too is the apparent increase in the size of the bridging capacitor, $C_{\mu}$ or $C_{g d}$. Thus $\omega_{\mathrm{HI}}$ is larger for the degenerate-emitter and degenerate-source stages, but what is gained in a wider mid-band frequency range is lost in lower gain. The product of the two, called the gain-bandwidth product, is essentially unchanged.

### 14.2.4 Emitter/Source-Follower

The capacitor connecting the input and output sides of the transistor (i.e., $C_{\mu}$ in the case of a bipolar transistor and $C_{g d}$ in the case of an FET) also plays an important role in the high-frequency performance of the emitter-follower or source-follower circuits, but it does not suffer Miller effect amplification in these circuits. Since in these circuits the collector and drain terminals are incrementally grounded, this capacitor appears directly across the input to the stage. This is illustrated for the emitter-follower in Fig. 14.6. In Fig. 14.6a the small-signal equivalent circuit is drawn for an emitter-follower amplifier with $C_{\pi}$ and $C_{\mu}$ included. In Fig. $14.4 b$ the circuit is redrawn to emphasize the point that $C_{\mu}$ appears across the input. (We again use the bipolar transistor circuit for the sake of discussion; a similar discussion can be presented for FET circuits.)

Recalling that $R_{L}^{\prime}$ looks like $\left(\beta_{F}+1\right) R_{L}^{\prime}$ when viewed from the input terminals of an emitter-follower amplifier, we realize that the open-circuit time constant

(a)


2
(b)

FIGURE 14.5
741 operational amplifier, showing the use of the Miller effect to monolithically integrate a compensating capacitor: (a) the circuit schematic, in which you should notice $C_{1}$ bridging $Q_{16} ;(b)$ a photomicrograph of the integrated-circuit chip with the terminals 1 through 7, and the capacitor $C_{1}$ labeled. (Photograph courtesy of P. Martin, T. McClure, and R. Perilli of M.I.T.; chip provided by J. Chernoff and D. Coan of Analog Devices.)


FIGURE 14.6
Incremental equivalent circuit for a generic emitter-follower stage including $C_{\pi}$ and $C_{\mu}$ : (a) circuit drawn in the normal manner; (b) circuit drawn to emphasize the effective placement of $C_{\mu}$ across the input terminals.
resistance in parallel with $C_{\mu}$ is essentially $R_{S}^{\prime}\left(\equiv R_{S}+r_{x}\right.$ ) in parallel with ( $\beta_{F} R_{L}^{\prime}+$ $r_{\pi}$ ), the latter being approximately just $\beta_{F} R_{L}^{\prime}$. Thus the breakpoint frequency associated with $C_{\mu}$ is essentially $\left(R_{S}^{\prime}+\beta_{F} R_{L}^{\prime}\right) / \beta_{F} R_{L}^{\prime} R_{S}^{\prime} C_{\mu}$. If $R_{S}^{\prime}$ is much smaller than $\beta_{F} R_{L}^{\prime}$, this frequency is approximately $1 / R_{S}^{\prime} C_{\mu}$. If, on the other hand, $R_{S}^{\prime}$ is much larger than $\beta_{F} R_{L}^{\prime}$, this frequency is approximately $1 / \beta_{F} R_{L}^{\prime} C_{\mu}$.

The open-circuit time constant resistance in parallel with $C_{\pi}$ is more complicated, but you should be able to show that it is essentially $\left(R_{S}^{\prime}+R_{L}^{\prime}\right) r_{\pi} /\left(\beta_{F} R_{L}^{\prime}+\right.$ $\left.R_{S}^{\prime}\right)$. Looking at this result we see that in the limit of large $\beta_{F} R_{L}^{\prime}$ and moderate $R_{S}^{\prime}$, it approaches $r_{\pi} / \beta_{F}$ and the breakpoint frequency is approximately $\beta_{F} / C_{\pi} r_{\pi}$, or $g_{m} / C_{\pi}$; in the limit of very large $R_{S}^{\prime}$, it approaches $r_{\pi}$ and the breakpoint frequency is $\beta_{F}$ times smaller.

The question now is, how do we compare all of these frequencies to see what limits the response of this stage, and, more fundamentally, how does this stage compare with the common-emitter stage? The way to proceed is to first note that in most situations, $R_{S}$ will be small and the two relevant time constants are $R_{S}^{\prime} C_{\mu}$ and $C_{\pi} / g_{m}$; consequently we have

$$
\begin{equation*}
\omega_{\mathrm{HI}}(\text { emitter-follower }) \approx \frac{1}{R_{S}^{\prime} C_{\mu}+\left(\frac{C_{\pi}}{g_{m}}\right)}=\frac{g_{m}}{C_{\pi}+g_{m} R_{S}^{\prime} C_{\mu}} \tag{14.12a}
\end{equation*}
$$

Comparing this to $\omega_{\mathrm{HI}}$ for a common-emitter, Eq. (14.11), we see that $\omega_{\mathrm{HI}}$ for the emitter-follower is much higher because $g_{m} \gg g_{\pi}$. In situations where $R_{S}^{\prime}$ is very large, we have

$$
\begin{equation*}
\omega_{\mathrm{HI}}(\text { emitter-follower }) \approx \frac{1}{\beta R_{L}^{\prime} C_{\mu}+\left(\frac{C_{\pi}}{g_{\pi}}\right)}=\frac{g_{\pi}}{\left(C_{\pi}+g_{m} R_{L}^{\prime} C_{\mu}\right)} \tag{14.12b}
\end{equation*}
$$

This breakpoint is closer to that of the common-emitter, (Eq. 14.11), and in fact looks to be a bit lower until you also realize that if we are looking at a multistage amplifier to see, for example, which is the limiting stage, we would find that $R_{L}^{\prime}$
for the common-emitter stage is much larger than $R_{L}^{\prime}$ for the emitter-follower. Thus the advantage of the emitter-follower is much greater than a superficial comparison of Eqs. (14.11) and (14.12b) would indicate. We can conclude that the emitter-follower stage is in general much faster than the common-emitter stage.

The source-follower stage, pictured in Fig. 14.7, is also straightforward to analyze and leads us to similar conclusions. Doing an open-circuit time constant analysis we see that the resistance in parallel with $C_{g d}$ is $R_{T}$ and that in parallel with $C_{g s}$ is $\left(R_{L}^{\prime}+R_{T}\right) /\left(1+g_{m} R_{L}\right)^{\prime}$. The latter resistance is smaller, but $C_{g s}$ is larger than $C_{g d}$, so it is hard to say in general which is the larger time constant (and thus lower breakpoint frequency). We must combine them to estimate $\omega_{\mathrm{HI}}$ as

$$
\begin{equation*}
\omega_{\mathrm{HI}}(\text { source-follower }) \geq \frac{1}{R_{T} C_{g d}+\left[\left(R_{L}^{\prime}+R_{T}\right) / 1+g_{m} R_{L}^{\prime}\right] C_{g s}} \tag{14.13a}
\end{equation*}
$$

Multiplying the numerator and denominator by $\left(1+g_{m} R_{L}^{\prime}\right) G_{T}$ we get a form we can compare with our common-source result, Eq. (14.9a):

$$
\begin{equation*}
\omega_{\mathrm{HI}}(\text { source-follower }) \geq \frac{\left(1+g_{m} R_{L}^{\prime}\right) G_{T}}{\left(1+R_{L}^{\prime} G_{T}\right) C_{g s}+\left(1+g_{m} R_{L}^{\prime}\right) C_{g d}} \tag{14.13b}
\end{equation*}
$$

Clearly this is a higher frequency, by a factor of at least $\left(1+g_{m} R_{L}^{\prime}\right)$, and we can conclude that the source-follower stage is in general much faster than the common-source stage.

### 14.2.5 Common-Base/Gate

The common-base/gate stage is particularly easy to analyze because there are no capacitors in feedback positions (i.e., coupling the input and output), as can be seen by examining Fig. 14.8. We can readily apply the open-circuit time constant method to this circuit and calculate the time constants associated with $C_{\pi}$ and $C_{\mu}$ as

$$
\begin{equation*}
\omega_{\pi}=\frac{\left(g_{e}+G_{S}^{\prime}\right)}{C_{\pi}} \approx \frac{g_{m}}{C_{\pi}} \tag{14.14a}
\end{equation*}
$$



FIGURE 14.7
Incremental equivalent circuit for a source-follower stage including $C_{g s}$ and $C_{g d}$.


FIGURE 14.8
Incremental equivalent circuit for a generic common-base stage including $C_{\pi}$ and $C_{\mu}$.

$$
\begin{equation*}
\omega_{\mu}=\frac{1}{R_{L}^{\prime} C_{\mu}} \tag{14.14b}
\end{equation*}
$$

Notice that in the second expression for $\omega_{\pi}$ we have used the fact that $g_{e}$ is approximately $g_{m}$ and have neglected $G_{S}$ relative to $g_{m}$ (see the last footnote on page 470 for a justification of this). Combining these two frequencies, we have

$$
\begin{equation*}
\left.\omega_{\mathrm{HI}}(\text { common-base }) \geq \frac{1}{R_{L}^{\prime} C_{\mu}+\left(C_{\pi} / g_{m}\right)}=\frac{g_{m}}{\left(C_{\pi}+g_{m} R_{L}^{\prime} C_{\mu}\right.}\right) \tag{a}
\end{equation*}
$$

Comparing this to the common-emitter result, Eq. (14.11), we see that this $\omega_{\mathrm{HI}}$ is $\beta_{F}$ times larger, since $g_{m}=\beta_{F} g_{\pi}$. That is,

$$
\begin{equation*}
\omega_{\mathrm{HI}}(\text { common-base }) \approx \beta_{F} \omega_{\mathrm{HI}}(\text { common-emitter }) \tag{14.15b}
\end{equation*}
$$

The incremental equivalent circuit for a common-gate stage with the substrate grounded is illustrated in Fig. 14.9. We can see by inspection that the conductance in parallel with $C_{g s}$ is $(1+\eta) g_{m}+G_{T}$ and that the resistance in parallel with $C_{g d}$ is $R_{L}^{\prime}$. Thus we have

$$
\begin{equation*}
\omega_{\mathrm{HI}}(\text { common-gate }) \geq \frac{1}{R_{L}^{\prime} C_{g d}}+\frac{g_{m}+G_{T}}{C_{g s}}=\frac{g_{m}+G_{T}}{C_{g s}+\left(g_{m}+G_{T}\right) R_{L}^{\prime} C_{g d}} \tag{14.16}
\end{equation*}
$$



FIGURE 14.9
Incremental equivalent circuit for a common-gate stage with a grounded substrate including $C_{g s}$ and $C_{g d}$.

Comparing this to the common-source result, Eq. (14.9a), we see that it is larger by a factor of $\left(1+g_{m} / G_{T}\right)$, which can often be substantial since, as we have said, $G_{T}$ is often much less than $g_{m}$.

Comparing the common-base/gate, common-emitter/source, degenerateemitter/source, and emitter/source-follower stages, we see that the common-base/ gate stage and the emitter/source-follower stage have the best high-frequency response.

### 14.2.6 Cascode

We are now in a position to appreciate the logic behind the cascode configuration we first considered in Sec. 13.2.2. In the cascode the first stage is a commonemitter or common-source stage that has only a small voltage gain, but we now see that this also means there will be a very small Miller effect on this stage and the magnitude of the stage's high-frequency breakpoint will be increased. The second stage, which provides the cascode's voltage gain, is a common-base or common-gate stage that has an inherently large high-frequency breakpoint. Thus the composite cascode amplifier has high gain up to a considerably higher frequency than would a simple common-emitter or common-source stage.

To quantify these points, consider the MOSFET cascode in Fig. 14.10a and its small-signal equivalent circuits in Figs. $14.10 b$ (mid-band) and 14.10 c (midand high-frequencies). Referring first to the mid-band circuit, we can see that $g_{m 2}^{\prime} v_{g s 2}$ is equal to $g_{m 1} v_{g s 1}$, so the two dependent current sources turn out to be equal.* Thus the first-stage voltage gain $v_{s g 2} / v_{g s 1}$ (note the order of the subscripts) is $-g_{m 1} / g_{m 2}^{\prime}$, which is also $-\left(K_{1} / K_{2}\right)^{1 / 2}$ divided by $(1+\eta)$ since $Q_{2}$ and $Q_{1}$ have equal quiescent drain currents. The second-stage voltage gain $v_{\text {out }} / v_{s g 2}$ is $-g_{m 2}^{\prime} R_{D}$, and thus the cascode voltage gain $v_{\text {out }} / v_{g s 1}$, is $-g_{m 1} R_{D}$, which is the same as the gain of a common-source stage biased and loaded similarly. We, of course, essentially knew this result already from Sec. 13.2.2.

Looking now at the high-frequency model, Fig. 14.10 c , we see that the Miller effect on the first stage for which $A_{\nu}$ is only -1 , assuming $K_{1}=K_{2}$, is to double $C_{8 d 1}$. In contrast, in a common-source stage the Miller effect would effectively increase $C_{g d}$ as seen from the input by a factor of $g_{m} R_{D}$, which is undoubtedly much greater than 2 .

Looking back at our analysis of the bipolar cascode in Sec. 13.2.2, we see that the first-stage voltage gain there was also -1 , so again the Miller effect multiplication factor on the $C_{\mu}$ of the first stage is only 2 .

If you have been alert you will have noticed that the magnitude of the voltage gain of the first stage of the MOSFET cascode can actually be less than 1 if $K_{2}$ is larger than $K_{1}$, and we can easily make this the case by making $Q_{2}$ wider than $Q_{1}$ (i.e., $W_{2}>W_{1}$ ). Making $K_{2}$ bigger than $K_{1}$ does not change the overall gain, but it does reduce the Miller effect even further. In the bipolar cascode the first-stage voltage gain is -1 independent of the transistor $\beta_{F}$-valves, (assuming

[^22]
(a)

(b)

(c)

FIGURE 14.10
MOSFET cascode: (a) the circuit schematic; (b) the mid-band small-signal equivalent circuit; $(c)$ the small-signal equivalent circuit useful at mid and high frequencies and, in particular, for determining the upper mid-band bound.
they are large, of course), so we cannot use a similar trick to reduce the Miller effect multiplier below 2 in the bipolar cascode.

### 14.2.7 Darlington Pair

The traditional Darlington pair that we studied in Sec. 13.2.3 and was pictured in Fig. $13.6 b$ is usually used in a common-emitter stage and thus suffers from the Miller effect typical of the common-emitter topology. The situation is worse with a Darlington than with a single transistor, however, because of the large input resistance of the Darlington pair and the fact that the Darlington pair is usually driven from a relatively high-output-resistance stage. These large resistances are in parallel with the Miller effect-multiplied $C_{\mu}$ of the first transistor, $C_{\mu 1}$; the resulting RC time constant is relatively much larger, and $\omega_{\mathrm{HI}}$ is relatively much lower than for a single-transistor common-emitter stage.

The high-frequency performance of the Darlington connection can be improved by connecting the collector of the first transistor $Q_{1}$ to the power supply and by adding an emitter resistor $R_{E 1}$ to the first transistor; these changes were illustrated in Fig. 13.9. To see why these changes increase $\omega_{\mathrm{HI}}$, refer to Fig. 14.11, which compares the small-signal linear equivalent circuits for the


FIGURE 14.11
Small-signal high-frequency linear equivalent circuits for two different versions of the Darlington pair: (a) the equivalent circuit of the basic Darlington shown in Fig. $13.6 b ;(b)$ the equivalent circuit of the improved Darlington connection shown in Fig. 13.9.
"traditional" and the "improved" Darlington connections. In the improved connection, shown in Fig. 14.11b, the first stage is an emitter-follower and there is minimal Miller multiplication of $C_{\mu 1}$. At the same time, $r_{\pi 1}$ is much lower in this connection because of the presence of $R_{E 1}$, which increases the quiescent collector current
of $Q_{1}, I_{C 1}$; thus the RC time constant associated with $C_{\mu 1}$ is much smaller and the pole frequency $\omega_{j}$ is much higher here than in the traditional Darlington. The only appreciable Miller effect in the improved configuration is that associated with $C_{\mu 2}$. The resistance seen by the Miller-multiplied $C_{\mu 2}$ is the parallel combination of $r_{\pi 2}, R_{E 1}$, and $\left(r_{\pi 1}+R_{S}\right) / \beta$, where $R_{S}$ is the equivalent source resistance (see Eq. 14.4a). Since $r_{\pi 1}$ is now much smaller than before, the later factor typically dominates the resistance and the RC time constant associated with $C_{\mu 2}$ is much smaller than in the traditional Darlington connection.

### 14.3 INTRINSIC HIGH-FREQUENCY LIMITS OF TRANSISTORS

We have seen in the preceding sections that both the transistor and the circuit configuration in which it is used affect the high-frequency breakpoint of an amplifier. Device designers often want figures of merit for their devices that are independent of any particular circuit and are somehow intrinsic to the device. It is the challenge of the circuit designer to find a circuit topology that can extract as much of the intrinsic performance capability as possible.

In this section we will consider intrinsic high-frequency figures of merit for bipolar transistors first and then for field effect transistors.

### 14.3.1 Bipolar Transistors

The first figures of merit for the high-frequency performance of bipolar transistors will concern the common-emitter configuration. Recalling our discussion in Sec. 14.2.2, we saw that the Miller effect reduced the high-frequency breakpoint. The Miller effect can be reduced and $\omega_{\mathrm{HI}}$ increased by making $R_{L}$ as small as possible and by making $R_{S}$ as large as possible (i.e., making $G_{S}$ small). Both actions reduce the voltage gain of the circuit, however, and at first seem uninteresting. However, a bit more thought shows us that although the voltage gain is reduced, the current gain of the stage stays large (i.e., nearly $\beta_{F}$ ) and the stage is still useful.

Such observations lead us to define a short-circuit common-emitter current gain and to take its high-frequency breakpoint as a figure of merit for bipolar transistors. The concept is illustrated in Fig. 14.12a; a current source is applied to the input, and the output is short-circuited.* The short-circuit common-emitter current gain $\beta(j \omega)$ is defined as

$$
\begin{equation*}
\beta(j \omega) \equiv \frac{i_{c}(j \omega)}{i_{b}(j \omega)} \tag{14.17}
\end{equation*}
$$

[^23]

FIGURE 14.12
Small-signal linear equivalent circuits: (a) appropriate for calculating the short-circuit common-emitter current gain; $(b)$ appropriate for calculating the short-circuit common-base current gain.

Referring to Fig. 14.12, we find that $\beta(j \omega)$ can be written as

$$
\begin{equation*}
\beta(j \omega)=\frac{\left(g_{m}-j \omega C_{\mu}\right)}{\left[g_{\pi}+j \omega\left(C_{\pi}+C_{\mu}\right)\right]} \tag{14.18}
\end{equation*}
$$

At low frequencies, $\beta(j \omega)$ reduces to $g_{m} / g_{\pi}$, or $\beta_{F}$. The high-frequency breakpoint is clearly at $g_{\pi} /\left(C_{\pi}+C_{\mu}\right)$. We define this breakpoint as $\omega_{\beta}$. Thus

$$
\begin{equation*}
\omega_{\beta}=\frac{g_{\pi}}{\left(C_{\pi}+C_{\mu}\right)} \tag{14.19}
\end{equation*}
$$

It can be argued that the transistor is useful above $\omega_{\beta}$ because the magnitude of the short-circuit current gain is still greater than 1 . We thus define another frequency figure of merit $\omega_{T}$, which is the frequency at which the magnitude of $\beta(j \omega)$ is 1 . Examination of Eq. (14.18) shows us that

$$
\begin{equation*}
\omega_{T}=\left[\frac{g_{m}^{2}-g_{\pi}^{2}}{\left(C_{\pi}+C_{\mu}\right)^{2}-C_{\mu}^{2}}\right]^{1 / 2} \tag{14.20a}
\end{equation*}
$$

This can be simplified by realizing that $g_{m}^{2}-g_{\pi}^{2}$ is essentially $g_{m}^{2}$, and by using the fact that $C_{\pi}$ is typically much larger than $C_{\mu}$ and thus that $\left(C_{\pi}+C_{\mu}\right)^{2}-C_{\mu}^{2}$ is essentially $\left(C_{\pi}+C_{\mu}\right)^{2}$. Thus $\omega_{T}$ can be approximated as

$$
\begin{equation*}
\omega_{T} \approx \frac{g_{m}}{\left(C_{\pi}+C_{\mu}\right)} \tag{14.20b}
\end{equation*}
$$

Comparing this result to Eq. (14.15) for $\omega_{\beta}$ we see that

$$
\begin{equation*}
\omega_{T} \approx \beta_{F} \omega_{\beta} \tag{14.21}
\end{equation*}
$$

Because it is so much larger than $\omega_{\beta}, \omega_{T}$ is the common-emitter high-frequency figure of merit usually quoted for bipolar transistors.

Notice next that like any of the parameters associated with a small-signal incremental equivalent circuit, $\omega_{T}$ (as well as $\omega_{\beta}$ ) depends on the bias point. Referring to Eq. (14.20b), we know that $g_{m}$ increases as the collector bias current $I_{C}$ is increased, so it seems possible that $\omega_{T}$ would also increase as $I_{C}$ is increased. It will, to a point, but there is a limit because $C_{\pi}$ also increases as $I_{C}$ increases. In particular, $C_{\pi}$ is the sum of the emitter-base junction depletion and diffusion capacitances. Using Eq. (8.65) for the latter component we can write

$$
\begin{equation*}
C_{\pi}=g_{m} \tau_{b}+C_{\mathrm{e}-\mathrm{b}, \mathrm{depl}} \tag{14.22a}
\end{equation*}
$$

where $g_{m}$ is $q\left|I_{C}\right| / k T$ and $\tau_{b}$ is $\left(w_{B}^{*}\right)^{2} / 2 D_{\min , B}$. Clearly as $I_{C}$ is made larger and larger, the depletion capacitance contribution to $C_{\pi}$ will become unimportant and $C_{\pi}$ can be approximated as

$$
\begin{equation*}
C_{\pi} \approx g_{m} \tau_{b} \quad \text { for } I_{C} \text { large } \tag{14.22b}
\end{equation*}
$$

At such a large bias level, the base-collector junction depletion capacitance $C_{\mu}$ can also be neglected and $\omega_{T}$ approaches the limit

$$
\begin{equation*}
\omega_{T} \approx \frac{1}{\tau_{b}} \quad \text { for } I_{C} \text { large } \tag{14.23}
\end{equation*}
$$

We know from Sec. 14.2 that the common-base stage has a higher highfrequency response than the common-emitter stage, so it is natural that we next consider the high-frequency breakpoint of the short-circuit common-base current gain $\alpha(j \omega)$. The idea is illustrated in Fig. 14.12b. We define $\alpha(j \omega)$ as follows:

$$
\begin{equation*}
\alpha(j \omega) \equiv-\frac{i_{c}(j \omega)}{i_{e}(j \omega)} \tag{14.24}
\end{equation*}
$$

Referring to Fig. $14.12 b$, we see that

$$
\begin{equation*}
\alpha(j \omega)=\frac{g_{m}}{\left(g_{\pi}+g_{m}+j \omega C_{\pi}\right)} \tag{14.25}
\end{equation*}
$$

At low frequencies this is clearly $\alpha_{F}$ and the high-frequency breakpoint, which we will define as $\omega_{\alpha}$, is

$$
\begin{equation*}
\omega_{\alpha}=\frac{\left(g_{\pi}+g_{m}\right)}{C_{\pi}} \tag{14.26a}
\end{equation*}
$$

or, assuming $\beta_{F}$ is much greater than 1 ,

$$
\begin{equation*}
\omega_{\alpha} \approx \frac{g_{m}}{C_{\pi}} \tag{14.26b}
\end{equation*}
$$

In the limit of large collector current bias levels, $\omega_{\alpha}$ approaches the same bound as did $\omega_{\beta}$; that is, we have

$$
\begin{equation*}
\omega_{\alpha} \approx \frac{1}{\tau_{b}} \text { for } I_{C} \text { large } \tag{14.27}
\end{equation*}
$$

Comparing Eqs. (14.19), (14.20b), and (14.26a), we see that we have the following relationship between the various figures of merit we have identified:

$$
\begin{equation*}
\omega_{\alpha}>\omega_{T} \gg \omega_{\beta} \tag{14.28}
\end{equation*}
$$

We should also note that since $\tau_{b}$ varies inversely with $D_{\min , B}, n p n$ transistors will be faster than $p n p$ transistors. It is furthermore clear that it is very desirable to make $w_{B}$ as small as possible to further reduce $\tau_{b}$.

At this point it is appropriate to finally look back at our assumption of quasistatic conditions for purposes of obtaining solutions to the flow problems we set up in the quasineutral regions of our transistors. Can we simultaneously have a quasistatic problem and high-frequency operation? Since "quasistatic" and "highfrequency" are not absolutes but must always be considered in an appropriate context, the answer can certainly be yes, but this is something that must be checked.

To proceed, we note that both $\omega_{\alpha}$ and $\omega_{T}$ approach, but are always less than, $\left(\tau_{b}\right)^{-1}$, where $\tau_{b}$ can be interpreted as the average time it takes a minority carrier to transit the base. The argument then is that if the minority carriers can get across the base fast enough to adjust the quasistatic minority carrier profiles quickly enough for them to keep up with the signal voltages, then the structure looks static (i.e., it is quasistatic). Clearly, we are very close to the limit where this is no longer true, but not quite.

### 14.3.2 Field Effect Transistors

In a manner analogous to the one in which we obtained intrinsic high-frequency figures of merit for a bipolar transistor by calculating the device's short-circuit current gain, we evaluate field effect transistors. In particular, we calculate the common-source short-circuit current gain $\beta(j \omega)$ and define an $\omega_{T}$ that is the frequency at which the magnitude of $\beta(j \omega)$ is 1 .

The appropriate small-signal equivalent circuit for determining $\beta(j \omega)$ when $v_{b s}$ is zero is shown in Fig. 14.13. The capacitance $C_{g s}^{\prime}$ in this figure is defined to be $C_{g s}+C_{g b}$. A bit of algebra leads us to

$$
\begin{equation*}
\beta(j \omega)=\frac{\left(g_{m}-j \omega C_{g d}\right)}{j \omega\left(C_{g s}^{\prime}+C_{g d}\right)} \tag{14.29}
\end{equation*}
$$



FIGURE 14.13
Small-signal linear equivalent circuit used to calculate the short-circuit common-source current gain of a field effect transistor in saturation. The incremental substrate-to-source voltage $v_{b s}$ has been assured to be zero.

This expression has a rather different frequency dependence than did the shortcircuit common-emitter current gain, Eq. (14.18), in that its maximum magnitude occurs at $\omega=0$. Its magnitude decreases with increasing $\omega$ until $\omega$ is greater than the zero of the numerator, which occurs when $\omega$ is $g_{m} / C_{g d}$. By then, however, the magnitude of $\beta(j \omega)$ is much less than 1 because it approaches $C_{g d} /\left(C_{g s}^{\prime}+C_{g d}\right)$ and typically $C_{g s}^{\prime}$ is much larger than $C_{g d}$.

The frequency at which the magnitude of $\beta(j \omega)$ is 1 , which we call $\omega_{T}$ for a field effect transistor, is

$$
\begin{equation*}
\omega_{T}=\left[\frac{g_{m}^{2}}{\left(C_{g s}^{\prime}+C_{g d}\right)^{2}-C_{g d}^{2}}\right]^{1 / 2} \tag{14.30a}
\end{equation*}
$$

In practice $C_{g s}^{\prime}$ is typically much larger than $C_{g d}$, and in such cases $\omega_{T}$ can be approximated as follows:

$$
\begin{equation*}
\omega_{T} \approx \frac{g_{m}}{C_{g s}^{\prime}} \tag{14.30b}
\end{equation*}
$$

We didn't need to model the FET gate capacitances $\left(C_{g s}, C_{g d}\right.$, and $\left.C_{g b}\right)$ in detail when we first introduced them in Chap. 10, but now it is useful to obtain more detailed expressions for them. To calculate these capacitances we first need to find an expression for the gate charge $q_{G}$ as a function of $v_{G S}, v_{D S}$, and $v_{B S}$. The capacitances we seek will then be the derivatives of $q_{G}$ with respect to the appropriate voltages, evaluated at the quiescent operating point. We will do these calculations now for a MOSFET, first because that is a very important device, but also because the mathematics for a MOSFET is more tractable than for a JFET or MESFET; nonetheless, the conclusions we will ultimately reach on the importance of the transit time are relevant to all FETs.

We will use the gradual channel approximation and ignore body effects when we need to use a specific MOSFET model, and we will restrict ourselves to gate
biases above threshold so that the MOSFET is not cut off. We can then say that the gate charge $q_{G}$ will be equal to the sum of the gate charge at threshold, $Q_{G T}$, plus the negative of the channel charge $q_{N}$; that is,

$$
\begin{equation*}
q_{G}=Q_{G T}-q_{N} \tag{14.31}
\end{equation*}
$$

The gate charge at threshold, $Q_{G T}$, consists of any gate charge at flatband, $Q_{G F B}$, plus the negative of the depletion region charge at threshold, $W L Q_{D}^{*}\left(0, v_{B S}\right)$, where $Q_{D}^{*}$ is given by Eq. (10.13):

$$
\begin{equation*}
Q_{D}^{*}\left(0, v_{B S}\right)=-\sqrt{2 \epsilon_{s i} q N_{A}\left(\left|2 \phi_{p}\right|-v_{B S}\right)} \tag{10.13}
\end{equation*}
$$

Above threshold this charge does not change with $v_{G S}$ or $\nu_{D S}$ (it does change with $v_{B S}$, however). We have

$$
\begin{equation*}
Q_{G T}=Q_{G F B}-W L Q_{D}^{*} \tag{14.32}
\end{equation*}
$$

The channel charge $q_{N}$ is the integral of the channel sheet charge density $q_{N}^{*}(y)$ over the area of the gate:

$$
\begin{equation*}
q_{N}=W \int_{0}^{L} q_{N}^{*}(y) d y \tag{14.33}
\end{equation*}
$$

where $q_{N}^{*}(y)$ is given by

$$
\begin{equation*}
q_{N}^{*}(y)=-C_{O X}^{*}\left[v_{G S}-v_{C S}(y)-V_{T}\left(v_{B S}\right)\right] \tag{14.34}
\end{equation*}
$$

This latter expression is Eq. (10.5') after the definition of $V_{T}$ in Eq. (10.12a) has been used to simplify it (we dropped the subscript $S$, also) and $\varepsilon_{o} / t_{0}$ has been replaced with $C_{O X}^{*}$.

To do the integral in Eq. (14.33) we need to know $v_{C S}(y)$. To find this we return to Eq. (10.4b), which we rewrite here:

$$
\begin{equation*}
i_{D}=-W \mu_{e} q_{N}^{*}(y) \frac{d v_{C S}}{d y} \tag{14.35}
\end{equation*}
$$

We substitute Eq. (14.34) for $q_{N}^{*}(y)$ to obtain

$$
\begin{equation*}
i_{D}=W \mu_{e} C_{O X}^{*}\left(v_{G S}-v_{C S}-V_{T}\right) \frac{d v_{C S}}{d y} \tag{14.36}
\end{equation*}
$$

This is the same expression we integrated to calculate the terminal characteristics in Chap. 10, but now instead of integrating from 0 to $L$ and from 0 to $v_{D S}$, we integrate from 0 to $y$ and from 0 to $v_{C S}(y)$ [with $v_{C S}(y)$ being the quantity we want].

We proceed as follows. Rewrite Eq. (14.36) as

$$
\begin{equation*}
\int_{0}^{y} i_{D} d y=\int_{0}^{v_{C S}(y)} W \mu_{e} C_{O X}^{*}\left(v_{G S}-v_{C S}-V_{T}\right) d v_{C S} \tag{14.37}
\end{equation*}
$$

and integrate to obtain

$$
\begin{equation*}
i_{D} y=W \mu_{e} C_{O X}^{*}\left[\left(v_{G S}-V_{T}\right) v_{C S}-\frac{v_{C S}^{2}}{2}\right] \tag{14.38}
\end{equation*}
$$

Solving this quadratic for $v_{C S}$, we find

$$
\begin{equation*}
v_{C S}(y)=\left(v_{G S}-V_{T}\right)-\sqrt{\left(v_{G S}-V_{T}\right)^{2}-\frac{2 i_{D} y}{Z \mu_{e} C_{O X}^{*}}} \tag{14.39}
\end{equation*}
$$

Using this in Eq. (14.34) we have

$$
\begin{equation*}
q_{N}^{*}(y)=-C_{O X}^{*} \sqrt{\left(v_{G S}-V_{T}\right)^{2}-\frac{2 i_{D} y}{Z \mu_{e} C_{O X}^{*}}} \tag{14.40}
\end{equation*}
$$

We are at last in a position to do the integral in Eq. (14.33). Doing the integral and substituting the resulting expression for $q_{N}$ into Eq. (14.31), we obtain the equation we seek for $q_{G}$ :

$$
\begin{equation*}
q_{G}=Q_{G T}-\frac{2}{3} \frac{\mu_{e}\left(W C_{O X}^{*}\right)^{2}}{2 i_{D}}\left\{\left[\left(v_{G S}-V_{T}\right)^{2}-\frac{2 i_{D} L}{C_{O X}^{*} \mu_{e} W}\right]^{\frac{3}{2}}-\left(v_{G S}-V_{T}\right)^{3}\right\} \tag{14.41}
\end{equation*}
$$

At this point it is easiest to look at independently evaluating this equation for biases in the saturation region and in the linear region.

In saturation, $i_{D}$ is $\mu_{e} W\left(v_{G S}-V_{T}\right)^{2} / 2 L$, so the first term in brackets in Eq. (14.41) is zero and $q_{G}$ becomes simply

$$
\begin{equation*}
q_{G}(\text { saturation })=Q_{G T}+\frac{2}{3} W L C_{O X}^{*}\left(v_{G S}-V_{T}\right) \tag{14.42}
\end{equation*}
$$

Calculating the gate capacitances, we find, assuming that $Q_{G T}$ and $V_{T}$ are constants,

$$
\begin{equation*}
C_{g s} \equiv \frac{\partial q_{G}}{\partial v_{G S}} \left\lvert\, Q=\frac{2}{3} W L C_{O X}^{*}=\frac{2}{3} C_{G} \quad\right. \text { in saturation } \tag{14.43}
\end{equation*}
$$

where we have defined $C_{G}$ to be $W L C_{O X}^{*}$ and

$$
\begin{equation*}
\left.C_{d s} \equiv \frac{\partial q_{G}}{\partial v_{D S}} \right\rvert\, Q=0 \quad \text { in saturation } \tag{14.44}
\end{equation*}
$$

We had said earlier that $C_{d s}$ should ideally be zero in saturation, and Eq. 14.44 just confirms that conclusion. Also, we see that $C_{g s}$ is proportional to $C_{O X}^{*}$ and to the gate area $W L$ as we had anticipated. The curious feature is the factor of $2 / 3$ but it should not be too surprising since the inversion layer charge is not uniform and neither is the gate charge. The charge store is thus less than that on a parallel-plate capacitor, and so is the capacitance.

In the linear region, $i_{D}$ is more complicated. Substituting our expression for it into Eq. (14.41) we find, after a bit of algebra,

$$
\begin{equation*}
q_{G} \text { (linear) }=Q_{G T}+\frac{2}{3} C_{G} \frac{\left(v_{G S}-V_{T}\right)^{3}-\left(v_{G D}-V_{T}\right)^{3}}{v_{G S}^{2}-2 V_{T}\left(v_{G S}-v_{G D}\right)-v_{G D}^{2}} \tag{14.45}
\end{equation*}
$$

Notice that we have written this expression as dependent on $v_{G S}$ and $\nu_{G D}$, rather than $v_{G S}$ and $v_{D S}$, because we find $C_{g d}$ by differentiating with respect to $v_{G D}$. Taking the derivatives, assuming $Q_{T}$ and $V_{T}$ are constants, we find

$$
\begin{equation*}
C_{g s}=\frac{2}{3} C_{G}\left\{\frac{3\left(V_{G S}-V_{T}\right)^{2}}{[\text { term }]}+\frac{\left[\left(V_{G D}-V_{T}\right)^{3}-\left(V_{G S}-V_{T}\right)^{3}\right]\left(2 V_{G S}-2 V_{T}\right)}{[\text { term }]^{2}}\right\} \tag{14.46}
\end{equation*}
$$

and

$$
\begin{equation*}
C_{g d}=\frac{2}{3} C_{G}\left\{\frac{3\left(V_{G D}-V_{T}\right)^{2}}{[\text { term }]}+\frac{\left[\left(V_{G D}-V_{T}\right)^{3}-\left(V_{G S}-V_{T}\right)^{3}\right]\left(2 V_{G S}-2 V_{T}\right)}{[\text { term }]^{2}}\right\} \tag{14.47}
\end{equation*}
$$

Where [term] in the denominator denotes $\left[V_{G S}^{2}-2 V_{T}\left(V_{G S}-V_{G D}\right)-V_{G D}^{2}\right]$.
These expressions do show us that everything is still proportional to $C_{G}$, but beyond that they are more "inciteful" than insightful. Fortunately we can learn more by looking at them in two limits: first, for bias points near the saturation point (i.e., $V_{D S} \approx V_{G S}-V_{T}$ ) and, second, for bias points near the origin (i.e., $V_{D S} \approx 0$ ).

Near saturation we find

$$
\begin{array}{ll}
C_{g s} \approx \frac{2}{3} C_{G} & \text { when } V_{D S} \approx V_{G S}-V_{T} \\
C_{g d} \approx 0 & \text { when } V_{D S} \approx V_{G S}-V_{T} \tag{14.49}
\end{array}
$$

This is consistent with what we know must be the case in saturation, that is, Eqs. (14.43) and (14.44).

For small $V_{D S}$, multiple applications of L'Hôpital's rule lead us to the following conclusion:

$$
\begin{align*}
& C_{g s}=\frac{1}{2} C_{G} \quad \text { when } V_{D S} \approx 0  \tag{14.50}\\
& C_{g d}=\frac{1}{2} C_{G} \quad \text { when } V_{D S} \approx 0 \tag{14.51}
\end{align*}
$$

Again this result makes sense. It tells us that when both ends of the channel are at the same potential, the structure is uniform and symmetrical and so we see the full oxide capacitance, now split equally between the source and drain.

Between these two limits, $C_{g s}$ will increase from $C_{G} / 2$ to $2 C_{G} / 3$ as $V_{D S}$ increases from 0 to $V_{G S}-V_{T}$, whereas $C_{d s}$ will decrease from $C_{G} / 2$ to zero.

Finally, before returning to Eq. (14.30b) and $\omega_{T}$, we should say a few words about $C_{g b}$. We have not bothered to calculate it because we made $v_{b s}$ zero and, equivalently, we assumed that $V_{T}$ and $Q_{G T}$ were constants. If $v_{b s}$ is not zero, then we not only should calculate $C_{g b}$, but we should also notice that $C_{g s}$ and $C_{g d}$ now include additional terms because of the variations of $V_{T}$ and $Q_{G T}$ with
$v_{B S}$ and thus with $v_{G S}$ since we will want to write $v_{B S}$ as $v_{G S}-v_{G B}$.* We have all the expressions we need to do this but will not pursue it further here.

Returning to $\omega_{T}$ in Eq. (14.30b), we see that in saturation, which is where we need to know $C_{g s}$, the gate-to-source capacitance is not a function of the bias current. At the same time, the transconductance $g_{m}$ increases as the square root of $I_{D}$ [see Eq. (10.42b)]. Thus we see that $\omega_{T}$ varies with the bias point and increases as $I_{D}$ is increased; specifically, it increases as the square root of $I_{D}$.

The term $\omega_{T}$ can also be interpreted as the inverse of a transit time, just as it was in a bipolar transistor. In this case the relevant transit time is the time required for a carrier in the channel to travel from the source end of the channel to the drain end. To see this recall that the transconductance in saturation can be written in terms of $\left(V_{G S}-V_{T}\right)$ as [see Eq. (10.42a) for $g_{m}$ and Eq. (10.11a) for $K$ ]:

$$
\begin{equation*}
g_{m}=\frac{W}{L} \mu_{e} \frac{\varepsilon_{o}}{t_{0}}\left(V_{G S}-V_{T}\right) \tag{14.52}
\end{equation*}
$$

Combining this expression and Eq. (14.43) for $C_{g s}$ in saturation into Eq. (14.30b) for $\omega_{T}$, we have

$$
\begin{equation*}
\omega_{T}=\frac{3 \mu_{e}\left(V_{G S}-V_{T}\right)}{2 L^{2}} \tag{14.53}
\end{equation*}
$$

Now, the voltage drop along the channel in saturation is ( $V_{G S}-V_{T}$ ), so the average electric field is $\left(V_{G S}-V_{T}\right) / L$, and the corresponding carrier velocity is $\mu_{e}\left(V_{G S}-\right.$ $\left.V_{T}\right) / L$. The transit time $\tau_{\mathrm{tr}}$ of carriers traveling from the drain to the source can thus be estimated by dividing the drain-to-source distance $L$ by this velocity, which yields

$$
\begin{equation*}
\tau_{\text {tr }} \approx \frac{L^{2}}{\mu_{e}\left(V_{G S}-V_{T}\right)} \tag{14.54}
\end{equation*}
$$

Comparing this result with $\omega_{T}$ in Eq. (14.53), we see that $\omega_{T}$ is proportional to, and for all practical purposes equal to, $\left(\tau_{\text {tr }}\right)^{-1}$.

Equation (14.53) is very instructive. It tells us that we gain big by reducing the channel length $L$. It also tells us we gain by having a high carrier mobility in the channel (i.e., $n$-channel is better than $p$-channel). And, it tells us that it is advantageous to bias the gate well above threshold. There are limits to making ( $V_{G S}-V_{T}$ ) large, however. In particular, the gate oxide may break down and, more fundamentally, the carrier velocity may saturate, putting a lower bound on the transit time. That is, if the saturation velocity is $s_{\text {sat }}$, the minimum transit time will be $L / s_{\text {sat }}$ and $\omega_{T}$ will be limited to less than roughly $s_{s \text { at }} / L$. Clearly we still want to make $L$ small, but now the increase in $\omega_{T}$ with decreasing $L$ will be only

[^24]linear rather than quadratic. We also want the highest possible $s_{\text {sat }}$, although in practice variations in $s_{\text {sat }}$ from material to material are modest.

### 14.4 SUMMARY

There are many computer programs available for analyzing circuit performance over wide frequency ranges. These circuits are widely used by circuit designers and engineers, but in this chapter we have concentrated on developing simplified methods of analysis that hopefully promote intuitive insight into what elements limit the performance of various circuit configurations, especially at high frequencies. We have seen, for example, that the inverse of the sum of the open-circuit time constants associated with each of the parasitic capacitors in a circuit yields a good estimate of $\omega_{\mathrm{HI}}$, the high-frequency boundary of the mid-band range. We have also pointed out that this sum is dominated by the largest of these time constants. Furthermore, we have seen that a capacitor in the Miller position (i.e., bridging from the input to the output of a stage) will appear magnified by the magnitude of the voltage gain of the stage at the input and is likely to play a major role in limiting $\omega_{\mathrm{HI}}$.

Looking at specific stages, we have found that the common-base/gate and emitter/source-follower stages do not suffer from the Miller effect and offer the best high-frequency performance, whereas the high-voltage-gain commonemitter/source stage offers the worst. We have also seen how the cascode configuration combines the common-emitter/source and common-base/gate stages to simultaneously achieve the high gain of the former and the large bandwidth of the latter.

Finally, we have considered the intrinsic high-frequency limitations of both bipolar transistors and MOSFETs. We have seen that both perform best at high bias current levels and that both are ultimately limited by the transit time of carriers through the active region of the device (i.e., from the emitter to the collector in a BJT and from the source to the drain in a MOSFET). This observation teaches us that devices in which electrons comprise the main signal current will be faster than those relying on holes, and it illustrates the value of reducing transistor base widths and gate lengths.

## PROBLEMS

14.1 Refer to the $p-n$ diode in Problem 7.7.
(a) Calculate the following small-signal model parameters for two bias points, $V_{A B}=0.25 \mathrm{~V}$ and $V_{A B}=0.5 \mathrm{~V}$.
(i) Small-signal conductance $g_{d}$
(ii) Small-signal depletion capacitance $C_{d p}$
(iii) Small-signal diffusion capacitance $C_{d f}$
(b) Sketch Bode plots of the magnitude and phase of the small-signal admittance of this diode for the two bias points in part a. Be careful to label the breakpoint frequencies.
(c) The quasistatic approximation is quite good as long as things change slowly relative to the time it takes carriers to move through the device, the so-called transit time $t_{\mathrm{t}}$.
(i) Find an expression for the transit time for holes crossing the $n$-side of this diode by approximating $t_{t \text { tr }}$ as the total number of excess holes on the $n$-side [i.e., the integral of $p^{\prime}(x)$ from 0 to $w_{n}$ ] divided by the total hole flux [i.e., $\left.F_{h}=J_{h} / q=D_{h} p^{\prime}(0) /\left(w_{n}-x_{n}\right)\right]$. Your answer should look like the expression after Eq. (7.44') on page 156.
(ii) Calculate $t_{\mathrm{tr}}$ for this diode.
(iii) Indicate $1 / t_{\text {tr }}\left(\equiv \omega_{\text {tr }}\right)$ on your Bode plots in part b , and comment on the validity of the quasistatic approximation at the two bias points in part a.
14.2 (a) Draw the low frequency incremental linear equivalent circuit of the capacitively coupled emitter-follower stage illustrated in Fig. 11.10a. Your circuit should include $C_{I}$ and $C_{O}$.
(b) Assuming a sinusoidal input signal $v_{t}(t)=V_{t} \sin \omega t$, find a literal expression for the transfer function $V_{\text {out }}(j \omega) / V_{t}(j \omega)$.
(c) Find numerical values for the poles of the transfer function, assuming $C_{I}=$ $1.5 \mu \mathrm{~F}, C_{O}=25 \mu \mathrm{~F}, R_{T}=4 \mathrm{k} \Omega, R_{E}=3.4 \mathrm{k} \Omega, R_{L}=50 \Omega, R_{B 1}=R_{B 2}=$ $40 \mathrm{k} \Omega, V_{C C}=8 \mathrm{~V}, \beta_{f}=200, V_{B E, O N}=0.6 \mathrm{~V}$, and $\left|V_{A}\right|=100 \mathrm{~V}$.
(d) Use the method of short-circuit time constants (i) to find the short-circuit time constant associated with each transistor $C_{I}$ and $C_{O}$, and (ii) to estimate $\omega_{\text {LO }}$.
(e) Compare the time constants you have calculated in part d with the poles you found in part c; discuss the similarities and differences.
14.3 In our analysis of the common-base/gate circuit in Sec. 14.2.5, we ignored the parasitic base resistance. This problem explores this issue further.
(a) Use the method of open-circuit time constants to find a numerical value for the high-frequency cutoff $\omega_{\mathrm{HI}}$ of the common-base amplifier shown in Fig. P14.3 when

$$
\begin{aligned}
C_{\pi} & =20 \mathrm{pF}, & & R_{S}=1 \mathrm{k} \Omega \\
C_{\mu} & =0.5 \mathrm{pF}, & & R_{L}=2 \mathrm{k} \Omega \\
r_{x} & =0, & & \beta_{F}=200
\end{aligned}
$$



## FIGURE P14.3

(b) Assume now that $r_{x} \neq 0$ and find expressions for the open-circuit time constants associated with $C_{\mu}$ and $C_{\pi}$.
(c) Find a numerical value for the high-frequency cutoff when $r_{x}=200 \Omega$.
14.4 How large is the Miller effect multiplier in a logic inverter? That is, approximately how much larger is the gate-to-drain, or base-to-collector, capacitive charge storage in an inverter stage, as the input is changed from $v_{\mathrm{LO}}$ to $v_{\mathrm{HI}}$ and the output switches from $v_{\mathrm{HI}}$ to $\nu_{\mathrm{LO}}$, because of the Miller effect?
14.5 The discussion in Sec. 14.2.7 provides explanation of the superior high-frequency performance of the "improved" Darlington connection (see Fig. 13.9), but leaves a lot of detail to the reader. In this problem you are encouraged to fill in some of that detail.
(a) Your understanding of a circuit is often influenced by how it is drawn. One way of configuring the small-signal high-frequency linear equivalent circuit for the improved Darlington is shown in Fig. 14.11b. Redraw this equivalent circuit, repositioning the $g_{m 1} v_{\pi 1}$ dependent current source in parallel with $R_{E 1}$ and repositioning $C_{\mu 1}$ in parallel with $v_{\mathrm{in}}$.
(b) The discussion in Sec. 14.2.7 notes that $r_{\pi 1}$ is smaller in the improved connection than in the basic connection. How do $C_{\pi 1}$ and $C_{\mu 1}$ differ in the two connections?
(c) Estimate the high-frequency breakpoint $\omega_{\mathrm{HI}}$ for the two circuits in Fig. 14.11, assuming that they are both connected to a $1-\mathrm{k} \Omega$ load and that their inputs are connected to a current source with an equivalent output resistance of $100 \mathrm{k} \Omega$. Both transistors have $\beta=200$, and $Q_{2}$ is biased at 1 mA . Assume that the base transit time is 10 ps , that $C_{\pi}$ is dominated by the diffusion capacitance component, that $C_{\mu}$ is 1 pF independent of bias, and that $R_{E}$ is $10 \mathrm{k} \Omega$.
(d) Based on your calculations in part $c$, which capacitor in each connection dominates the high-frequency performance?
(e) The equivalent circuits in Fig. 14.11 do not include $r_{o 1}$ and $r_{o 2}$. Justify or criticize this omission.
14.6 Look back at the transistor described in problem 8.1. This vertical structure is used in an integrated npn transistor that has a base-emitter junction that is $10 \mu \mathrm{~m}$ by $100 \mu \mathrm{~m}\left(10^{-5} \mathrm{~cm}^{2}\right)$ and a base-collector junction that is $20 \mu \mathrm{~m}$ by $125 \mu \mathrm{~m}$ ( $2.5 \times 10^{-5} \mathrm{~cm}^{2}$ ).
(a) Calculate the base transit time $\tau_{b}$ in this structure.
(b) Calculate $\omega_{T}$ for this transistor when $I_{C}=1 \mathrm{~mA}$ and $V_{C E}=10 \mathrm{~V}$.
(c) Repeat part b with (i) $I_{C}=0.1 \mathrm{~mA}$, and (ii) $I_{C}=10 \mathrm{~mA}$.
(d) Comment on your results in parts $b$ and $c$ above, and compare them with $1 / \tau_{b}$ from part a.
14.7 A common way for manufacturers to provide information on the small-signal highfrequency characteristics of their transistors is by quoting typical and minimum (or maximum) values for the current-gain bandwidth product ( $f_{T}$ ), the collector-base capacitance ( $C_{c b}$ ), and the emitter-base capacitance ( $C_{e b}$ ) under specified measurement conditions. For example, the following information might be given:
(a) Describe a procedure for obtaining $C_{\pi}$ in the high-frequency hybrid $\pi$ model from this information, and calculate a value for $i t$.
(b) Do the same as in part a for $C_{\mu}$.
(c) Calculate the base transit time, $\tau_{b}$ for this transistor.
14.8 In this problem we want to analyze the high-frequency performance of the emitter-follower/common-base combination illustrated in Fig. 13.10; we call this circuit an emitter-coupled cascode.
(a) Draw an incremental equivalent circuit for this amplifier that includes the $C_{\pi}$ and $C_{\mu}$ terms of $Q_{1}$ and $Q_{2}$.
(b) Estimate the open-circuit time constant associated with each $C_{\pi}$ and $C_{\mu}$, and indicate which if any can be expected to dominate $\omega_{\mathrm{HI}}$.
(c) The topology of the circuit you drew in part a is very similar to the corresponding circuit for the improved Darlington connection (illustrated in Fig. 14.11b), but the sizes of the elements and the location of $C_{\mu 2}$ are quite different. Compare the high-frequency models, and comment on the differences in terms of their impact on the high-frequency performance of the stages.
14.9 Active loads add capacitance as well as resistance at the output of an amplifier circuit. Determine the high-frequency incremental equivalent circuits, including parasitic capacitances, for each of the following, and give an expression for the capacitance in terms of the relevant small-signal transistor model signal parameters.
(a) The BJT load in Fig. 11.7a.
(b) The saturated enhancement mode MOSFET in Fig. 11.12a.
(c) The linear enhancement mode MOSFET in Fig. 11.12b.
(d) The depletion mode MOSFET in Fig. 11.12c.
(e) The complementary MOSFET in Fig. 11.12d.
14.10 We use half-circuit analysis techniques to simplify the analysis of symmetrical differential amplifier circuits. Consider now the implications of using a half-circuit to estimate the high-frequency breakpoint of a differential amplifier.
(a) How would the $\omega_{\mathrm{HI}}$ of a fully symmetrical differential amplifier be related to the $\omega_{\mathrm{HI}}$ you would calculate for the difference mode half-circuit of this amplifier?
(b) Clearly you would estimate a different $\omega_{\mathrm{HI}}$ if you used a common mode rather than a difference mode half-circuit. What does this mean?
14.11 A certain $n$-channel MOSFET has a channel length of 2 microns, a gate oxide thickness of 40 nm , and a channel mobility for electrons of $600 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}$. The threshold voltage is 1 V .
(a) What is the transit time of the electrons through this channel when $V_{G S}$ is 3 V ?
(b) What is $\omega_{T}$ for this transistor at the same bias?
(c) How do your answers in parts a and b change if the channel length is reduced to $1 \mu \mathrm{~m}$ and the gate oxide thickness is reduced to 30 nm ? Assume that when the gate oxide thickness is reduced, the mobility also decreases to $400 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}$.
(d) Calculate the minimum transit times for these two channels assuming $s_{\text {sat }}$ is $10^{7}$ $\mathrm{cm} / \mathrm{s}$. Calculate also what value of gate-to-source voltage $V_{G S}$ this transit time would correspond to if velocity saturation is not a factor (or if the saturation model of Eq. (10.77) is used); that is, find $V_{G S}$ in $\left(V_{G S}-V_{T}\right)=L s_{s a t} / \mu_{e}$.
(e) What limits us from biasing any MOSFETs to the point that the carrier velocity is saturated in the channel?
14.12 Several times in Chap. 11 we biased a MOSFET using a resistor $R_{G}$ between the drain and gate terminals of the MOSFET. Examples can be found in Fig. 11.15a and in problem 11.12. We saw then that making $R_{G}$ very large was important to achieving high gain and high input resistance, but we said nothing about what doing this does to the frequency response of the circuit. Using the circuit of problem 11.12, determine the impact of a finite $R_{G}$ on the $\omega_{\mathrm{HI}}$ of this stage.
14.13 For the circuit in problem 12.3 do the following:
(a) Calculate the high-frequency breakpoint of the differential mode gain. Assume ideal voltage source inputs (i.e., zero source resistance).
(b) Calculate the low-frequency breakpoint of the differential mode gain.
(c) Is the high-frequency breakpoint of the common mode gain higher or lower than the differential mode gain breakpoint? Explain your answer.

## CHAPTER 15

## DIGITAL BUILDING-BLOCK CIRCUITS

With this chapter we begin consideration of the application of bipolar and field effect transistors as switches to perform digital logic operations and to store digital information. These "digital" applications use the large-signal characteristics of transistors and take advantage of the fact that they are very nonlinear elements. They are thus quite different than those applications explored in Chaps. 11 through 14 , which made use of the incremental linearity of transistors and dealt with their use in circuits designed to linearly amplify small time-varying signals.

When we speak of working in the digital world, we are dealing with information in the form of integer numbers. This is in contrast to information in the form of signals that can have magnitudes falling anywhere on a continuously varying scale, as we use when we speak of dealing in the analog world. Thus, rather than processing information in the form of a time-varying signal $v_{I}(t)$ of arbitrary (within bounds) amplitude, we want to process information (it may be the same information) in the form of a series of numbers $v_{I}[n T]$ that represent the amplitude of the signal $v_{I}(t)$ at successive times $n T$ spanning the period in which we are interested. If the amplitude is recorded with enough precision and enough frequency, the time-varying, continuous analog signal $v_{I}(t)$ and the collection of digital values $v_{I}[n T]$ will contain essentially the same information and are equally "good" representations of the signal.

It has proven most useful in the electronic processing of digital information to use a binary system rather than a decimal, octal, or other number system. The choice of a number system has absolutely no impact on the precision of a number being represented, of course, but the binary system maps very nicely onto
the on/off states of a switch. It is also simple enough to be comprehensible and useful to human designers like you and me. Thus we will look specifically at digital circuits that work with binary signals and that thus use a number system with only two digits. We call these two digits zero (0) and one (1), or, equivalently, $L O$ and $H I$.

In the following sections we will first consider how transistors can be used as switches to perform digital (in particular, binary) logic functions. Then we will look at specific realizations of logic circuits made, first, with MOSFETs, and, then, with bipolar transistors. Finally, we will look at how transistor switches can be used to store binary information, and we will discuss representative memory cell designs.

### 15.1 GENERIC BINARY LOGIC CIRCUITS

The basic building block for circuits that manipulate and store binary information is the inverter. We will thus first look at this circuit in a very general form in this section and then study specific MOSFET and BJT realizations in Secs. 15.2 and 15.3 .

### 15.1.1 Generic Inverter

An inverter is a circuit that has a high, or large, output signal when the input signal is low, or small, and a small output signal when the input signal is large. This relationship is illustrated in Figs. 15.1a and $b$.

The inverter is the basic building block for logic gates and memory cells; complex logic circuits are composed of many inverter-based stages interacting with each other. Thus the output of one stage serves as the input to another simi-


FIGURE 15.1
Input/output relationship of a generic inverter stage: (a) with a low, or 0 , input; (b) with a high, or 1 input; (c) illustration of the self-consistency of the high and low input and output signals.
lar stage, and when we speak of a high input, we mean an input signal identical to the high output of an identical inverter stage with a low input. Similarly, when we speak of a low input, we mean an input signal identical to the low output of an identical inverter with a high input. It all sounds very circular, and it is, because that is exactly what we want and require. This relationship is illustrated in Fig. 15.1c.

The input and output signals can be either voltages or currents, and both types of inverters exist. As a practical matter, however, the majority of inverters are voltage-based and tend to look a great deal like common-emitter/source linear amplifier stages. In general, as is illustrated in Fig. 15.2a, they consist of one transistor, which acts like a switch and is called the driver device, and another element that we call a load. The basic idea is that with the input low, the switch is open, no current flows through the load, and the output voltage is high. With the input high, the switch closes, current flows through the load, and the output voltage is low. The switch, or driver, device is a transistor that does not conduct unless it is turned on by an input signal. Thus the driver can be either an enhancement mode FET, as we shall see in Sec. 15.2 and as Fig. $15.2 c$ illustrates, or a bipolar junction transistor, as we shall see in Sec. 15.3 and as shown in Fig. 15.2b. A depletion mode FET, on the other hand, is not an attractive choice as a driver.

### 15.1.2 Realizing Logic Functions with Inverters

We represent, or define, a logic operation by a truth table, which is a chart that specifies the output for each of a complete set of inputs. As an example, the truth table of an inverter is shown in Fig. 15.3 along with a generic inverter stage.


FIGURE 15.2
(a) Use of a generalized switch and load to achieve the inverter function; (b) specific transistor inverter using a bipolar junction transistor switch, or driver; (c) specific transistor inverter using an enhancement mode MOSFET driver.


FIGURE 15.3
(a) Generic inverter stage; (b) its truth table.

The basic inverter stage can be extended to perform more complicated logic operations by combining several different inputs via several coupled driver devices.

As a first example, consider the AND function and its inverse, the NAND function. The logic AND is a function for which the output is a 1 only if all of the inputs are 1 ; it is 0 otherwise. For NAND, the output is 0 only if all of the inputs are 1 ; it is 1 otherwise. The corresponding truth table is presented in Fig. 15.4a. We can realize the NAND by putting several drivers (one for each input) in series as illustrated in Fig. $15.4 b$ for a two-input gate. The output $V_{C}$ in Fig. $15.4 b$ represents the NAND output. Putting an inverter on the output yields the AND of the inputs. The output $V_{D}$ in Fig. $15.4 b$ represents the AND output.

Another important group of logic operations is the OR function and its inverse, the NOR function. The logic OR is a function for which the output is a 1 if any of the inputs is a 1 ; for the NOR the output is 0 if any inputs are 1 . The truth table for these two functions is presented in Fig. 15.4c. The output $V_{C}$ represents the NOR output, and $V_{D}$ represents the OR output. We can realize the NOR function by putting several drivers in parallel as illustrated in Fig. 15.4d. Again, OR is obtained by putting an inverter after a NOR gate.

Finally, we point out that once we have the AND and OR functions, it is possible to realize more complex functions by building on these two basic functions. Some complex functions can even be realized with a single gate by placing some drivers in parallel and some in series. For example, consider the truth table shown in Fig. 15.4e. A three-input gate realizing this truth table is shown in Fig. 15.4f.

The process of building up logic functions can go on indefinitely. That is not our purpose in this text, but the central role played by the basic inverter stage should be very clear to you. We will focus in Secs. 15.2 and 15.3 on inverter design, but in doing so we will in fact be laying the groundwork for the design of arbitrarily complex logic circuits.

| NAND/AND |  |  |  |
| :---: | :---: | :---: | :---: |
| Inputs |  | Outputs |  |
|  | $\nu_{B}$ | $v_{C}$ | $v_{D}$ |
| 0 | 0 | 1 | 0 |
| 0 | 1 | 1 | 0 |
| 1 | 0 | 1 | 0 |
| 1 | 1 | 0 | 1 |

(a)

NOR/OR

| Inputs |  | Outputs |  |
| :---: | :---: | :---: | :---: |
| $v_{A}$ | $v_{B}$ | $v_{C}$ | $v_{D}$ |
| 0 | 0 | 1 | 0 |
| 0 | 1 | 0 | 1 |
| 1 | 0 | 0 | 1 |
| 1 | 1 | 0 | 1 |

(c)

| Inputs |  |  |  |  | Outputs |  |
| :---: | :---: | :---: | :---: | :---: | :---: | :---: |
| $v_{A}$ | $v_{B}$ | $v_{C}$ | $v_{D}$ | $v_{E}$ |  |  |
| 0 | 0 | 0 | 1 | 0 |  |  |
| 0 | 0 | 1 | 1 | 0 |  |  |
| 0 | 1 | 0 | 1 | 0 |  |  |
| 0 | 1 | 1 | 1 | 0 |  |  |
| 1 | 0 | 0 | 1 | 0 |  |  |
| 1 | 0 | 1 | 0 | 1 |  |  |
| 1 | 1 | 0 | 0 | 1 |  |  |
| 1 | 1 | 1 | 0 | 1 |  |  |.

(e)

(b)

(d)

(f)

FIGURE 15.4
Logic operations based on expansion of an inverter stage: (a) the truth table of the AND and NAND functions; (b) the circuit realization of $(a) ;(c)$ the truth table of the OR and NOR functions; (d) the realization of (c); (e) a multioperation truth table; $(f)$ the circuit realization of (e).

### 15.1.3 Objectives in Inverter Design

We can identify several key characteristics of any inverter that provide useful criteria to guide the design of a specific inverter circuit. In particular there are the high and low voltage levels at which it operates; the speed at which it operates; the power that it consumes; the limitation to design trade-offs between speed and power, which is quantified through the power-delay product; the number of stages to which its output can be connected, a property we call its fan-out; the ease with which it can accept multiple inputs (its fan-in); the loading it presents preceding stages; its sensitivity to noise, which is quantified by quoting what are called its noise margins; and, finally, its size and complexity (i.e., its manufacturability). We will consider each of these characteristics in turn below.
a) High and low voltage levels. As was illustrated in Fig. 15.1c, the high and low voltage levels of an inverter have to satisfy a very particular relationship. Specifically, when the input is $V_{\text {LO }}$ the output must be $V_{\mathrm{HI}}$, where $V_{\mathrm{HI}}$ is the input that results in an output $V_{\text {Lo }}$. The first step in determining what these voltage levels are for a given inverter circuit is to determine the large-signal transfer characteristic of the circuit (i.e., $v_{\text {OUT }}$ versus $v_{\text {IN }}$ ). A typical example is sketched in Fig. 15.5a. With this information, the self-consistent set of high and low voltages we seek can readily be determined. Referring to Fig. 15.1c, we see that the input and output of the first inverter, $v_{\text {IN } 1}$ and $v_{\text {OUT1 }}$, must be related by the inverter transfer characteristic through the first stage:

$$
\begin{equation*}
v_{\mathrm{OUT} 1}=f\left(v_{\mathrm{IN} 1}\right) \tag{15.1}
\end{equation*}
$$

At the same time, $v_{\mathbb{N} 2}$ and $v_{\text {OUT2 }}$ must be related in the same way through the second stage:

$$
\begin{equation*}
v_{\mathrm{OUT} 2}=f\left(v_{\mathrm{IN} 2}\right) \tag{15.2a}
\end{equation*}
$$

However, since $v_{\mathrm{IN} 2}$ is $v_{\text {OUT1 }}$ and $v_{\mathrm{OUT} 2}$ is $\nu_{\mathrm{IN} 1}$, this last equation can also be viewed as another relationship between $v_{\text {IN } 1}$ and $v_{\text {OUT } 1}$; that is,

$$
\begin{equation*}
v_{\mathrm{IN} 1}=f\left(v_{\text {OUT } 1}\right) \tag{15.2b}
\end{equation*}
$$

Combining Eqs. (15.1) and (15.2b) yields a single equation to be solved for $v_{\mathrm{IN} 1}$ :

$$
\begin{equation*}
v_{\mathrm{IN} 1}=f\left[f\left(v_{\mathrm{IN} 1}\right)\right] \tag{15.3}
\end{equation*}
$$

The easiest and most instructive way to solve this expression is graphically, as is illustrated in Fig. 15.5b. The solid curve is Eq. (15.1), and the dashed curve is Eq. (15.2b). Their intersections represent solutions of Eq. 15.3. Looking at Fig. $15.5 b$, we see that there are three possible $v_{\mathrm{IN}}$ that satisfy Eq. (15.3) (and three corresponding values for $v_{\text {OUT }}$ ). Of these three solutions for $v_{\text {IN } 1}$, the lowest corresponds to $V_{\text {LO }}$, and the highest to $V_{\mathrm{HI}}$. The middle value $V_{\mathrm{TR}}$ is not a stable solution. (The "TR" stands for "trigger," a name that will become clear when we discuss noise margins below.)


FIGURE 15.5
(a) Transfer characteristic for a typical inverter stage; (b) graphical solution of Eq. (15.3) for a connection as in Fig. 15.1c.
b) Switching Speed. The switching speed of an inverter is the time it takes for the output to change from one state to another for a step change in the input. Clearly there are actually two switching times of interest, corresponding, respectively, to the input going from HI to LO and to the input going from LO to HI . In general these times will be different, in some cases quite different.

The switching times of an inverter are determined by the difference in the amounts of energy stored in the inverter elements in each of its two states. We know from our discussion of p-n junctions and MOS capacitors, for example, that there are numerous capacitive charge stores in any device and that the amount of charge stored in a device changes as the terminal voltage and state of the device change. Thus as a transistor is switched from off to on or on to off, these charge stores have to be either filled or emptied; we say charged or discharged. The time it takes to accomplish this charging and/or discharging determines in large part how quickly an inverter will switch from one state to the other (i.e., its switching speed).

The on-to-off switching time is determined predominantly by the load because the switch transistor is off and the output is changing from its low value to its high value. Any "charging up" of the output node must occur through the load device. If the dynamic load on this node can be modeled as a linear capacitor $C_{L}$ and the current supplied to this node through the load is $i_{L}$, we have

$$
\begin{equation*}
i_{L}=C_{L} \frac{d \nu_{\mathrm{OUT}}}{d t} \tag{15.4a}
\end{equation*}
$$

or rearranging,

$$
\begin{equation*}
\frac{d v_{\mathrm{OUT}}}{d t}=\frac{i_{L}}{C_{L}} \tag{15.4b}
\end{equation*}
$$

In general, $i_{L}$ will be a function of $v_{\text {OUT }}$, as we shall see when we look at specific inverter designs in Secs. 15.2 and 15.3.

The off-to-on switching time is determined by the switching, or driver, transistor, which must discharge the output node as it swings from $v_{\mathrm{HI}}$ to $v_{\mathrm{L} O}$. It conducts this discharge current as well as the load current, and thus we have the following expression relating the driver drain current and the output voltage:

$$
\begin{equation*}
i_{D D}=i_{L}-C_{L} \frac{d \nu_{\text {OUT }}}{d t} \tag{15.5a}
\end{equation*}
$$

which yields

$$
\begin{equation*}
\frac{d v_{O U T}}{d t}=-\frac{\left(i_{D D}-i_{L}\right)}{C_{L}} \tag{15.5b}
\end{equation*}
$$

In this expression both $i_{D D}$ and $i_{L}$ are functions of $v_{\text {OUT }}$, and in general $i_{D D}$ is much larger than $i_{L}$. In many inverters this transient is significantly faster than the on-to-off transient.

As we stated before writing Eq. (15.4a), the above equations are valid only if we can assume that the charge store can be modeled as an ideal linear capacitor, but the basic conclusions we have reached about the importance of the load current in charging the output note and of the difference between the driver and load currents in discharging it are quite general. So too is the idea that the rate at which the node charges (or discharges) will be directly proportional to the net current into (or out of) the node and inversely proportional to the amount of charge stored there. We will study all of these issues in much more detail in Chap. 16, which is devoted to analyzing switching transients and speed.
c) Power consumption. The power consumed by an inverter stage depends on its logic state, so we speak in terms of the average power an inverter consumes if it is, on average, in each state half of the time. Furthermore, an inverter will consume additional power each time it changes state because in doing so energy must be put into or taken out of the charge stores in the devices. Thus there is also a component of the average power consumption that depends on how frequently the inverter is being switched, that is, on the clock frequency. Putting these components together we have the following expression:

$$
\begin{equation*}
P_{\mathrm{AVE}}=\frac{1}{2} P_{\mathrm{ON}}+\frac{1}{2} P_{\mathrm{OFF}}+f_{\mathrm{CLOCK}} E_{\mathrm{CYCLE}} \tag{15.6}
\end{equation*}
$$

where $P_{\mathrm{ON}}$ and $P_{\mathrm{OFF}}$ are the average powers dissipated in the "on" and "off" states of the inverter, respectively, $f_{\text {CLOCK }}$ is the clock frequency, and $E_{\text {CYCLE }}$ is the energy dissipated each cycle in switching. The factors of $\frac{1}{2}$ in the first two terms assume that the inverter is on half of the time and off half of the time, as we have said, and that the switching time is a small fraction of the total cycle time.

If this is not true, these factors should be adjusted accordingly. Also, multiplying $E_{\text {CYCLE }}$ by $f_{\text {CLOCK }}$, rather than by a fraction of $f_{\text {CLOCK }}$, assumes that the inverter switches every cycle, which is clearly a worst-case assumption for an average gate.
d) Power-delay product. A little thought about the switching speed and power consumption discussion in the preceding two subsections will show you that both quantities vary in the same way with some design variables, such as the load current, and in opposite ways with others, such as the size of the charge store. In general we want to increase the speed of a circuit and decrease its power consumption, and because of the interdependence of these factors it is convenient to define a third quanitity that clearly shows us what our design options are (i.e., what we can do to improve performance in both respects and when we have to compromise). The parameter that is commonly used for this purpose is the powerdelay product. By "delay" we mean the minimum length of a complete logic cycle (i.e., the sum of the switching transients for the low-to-high and the high-to-low transitions). Clearly designing for maximum speed is equivalent to designing for minimum delay.

Forming the product of the average power consumption during a cycle and the minimum delay gives us a quantity we call the power-delay product. The power-delay product has the units of energy and is a useful parameter for understanding inverter design trade-offs.
e) Fan-in and fan-out. The fan-in of an inverter stage is the number of inputs it has. A simple inverter, of course, has only one input signal, but since we are looking at inverters as the basis of mulitple-input logic gates, as we did in Fig. 15.4, we will want to consider in each case how we can add multiple inputs for both NAND and NOR functions to a basic inverter stage and what effects these inputs have on the inverter performance.

The fan-out of an inverter stage is the number of similar stages that can be connected to its output and still allow the circuit to remain functional and to maintain useful high and low output levels. The fan-out thus depends in large part on how much input current the following stages require and how much output the inverter stage can supply. The switching speed of a stage will also be affected by the number of stages connected to its output, and this may place another restriction on the fan-out.

In practice fan-ins and fan-outs of 3 or 4 are usually adequate for an inverter design. A minimum of 2 is needed to do anything useful, and more than 4 is seldom required.
f) Noise margins. It is desirable from power considerations to keep the voltage levels in an inverter as low as possible. Considering what limits us in this regard, we typically find that the minimum power supply voltage is determined by the stability of the inverter states. There are random voltage and current fluctuations
in any electrical system, and this "noise" can inadvertently cause a chain of inverters (i.e., a series of gates) to change states if a fluctuation is large enough. The measure of how large a fluctuation must be to switch a given inverter out of a particular state is that state's noise margin.

We can find the noise margins of an inverter from its transfer characteristic. Referring to Fig. $15.5 b$, recall that there is a third solution for $v_{\mathrm{IN}}$ and $v_{\text {Out }}$ that we said was unstable and that fell between the two solutions we selected as determining $V_{\mathrm{LO}}$ and $V_{\mathrm{HI}}$. This third solution, $v_{\mathrm{IN}}=v_{\mathrm{OUT}}=V_{\mathrm{TR}}$, is unstable because any slight fluctuation of $v_{\mathrm{IN}}$ away from this value $V_{T R}$ causes the circuit to switch to one of the other two solutions (which one depends on the sign of the fluctuation). This is important because if we now consider ourselves to be at one of the two stable solution points and a voltage fluctuation occurs that is large enough to push us momentarily past the unstable point $V_{\mathrm{TR}}$, the inverter will inadvertently switch states.

When we have several inverters connected in a chain, the fluctuations can be amplified through the chain if the magnitude of the incremental voltage gain exceeds 1 . Thus even though the initial fluctuation is not large enough to push us past $V_{\mathrm{TR}}$, it may become large enough to switch a later stage; thus the critical margins are the voltage differences between $V_{\mathrm{LO}}$ and $V_{\mathrm{HI}}$ and the nearest points on the transfer characteristic at which the magnitude of the slope (i.e., the gain) exceeds 1. These points are labeled $V_{1 L}$ and $V_{1 H}$ on Fig. 15.6. We define the low and high state noise margins, $\mathrm{NM}_{\mathrm{LO}}$ and $\mathrm{NM}_{\mathrm{HI}}$, as $\left(V_{1 L}-V_{\mathrm{LO}}\right)$ and $\left(V_{\mathrm{HI}}-V_{1 H}\right)$, respectively. That is

$$
\begin{equation*}
\mathrm{NM}_{\mathrm{LO}}=\left(V_{1 L}-V_{\mathrm{LO}}\right) \tag{15.7a}
\end{equation*}
$$

and

$$
\begin{equation*}
\mathrm{NM}_{\mathrm{HI}}=\left(V_{\mathrm{HI}}-V_{1 H}\right) \tag{15.7b}
\end{equation*}
$$

It should be clear that we want the two noise margins to be equal and as large as possible. Optimally, then, we want to design our inverter to have as sharp and steep a transfer characteristic as possible, and to have the steep portion centered midway between $V_{\mathrm{HI}}$ and $V_{\mathrm{LO}}$. This latter feature is consistent with designing $V_{T R}$ to be approximately $\left(V_{\mathrm{HI}}+V_{\mathrm{LO}}\right) / 2$.
g) Manufacturability. As important as all of the performance considerations we have just outlined are concerns about building integrated circuits based on a given inverter design. We call this manufacturability. It is affected by such factors as the complexity of the circuit and of the process required to fabricate it, the size of the building-block circuits and the number of building-block units required to realize the logic functions of interest, and the tolerance of the design to process variations. We will not attempt to give an exhaustive treatment of these issues here, but we will comment on them from time to time, and it is important that you be sensitive to them.


FIGURE 15.6
Transfer characteristics for a typical inverter stage with the points of unity incremental voltage gain, $V_{1 L}$ and $V_{1 H}$, identified and with the high and low noise margins, $\mathrm{NM}_{\mathrm{HI}}$ and $\mathrm{NM}_{\mathrm{LO}}$, respectively, indicated.

### 15.1.4 Determining the Transfer

## Characteristic

It is clear from the preceding discussion of inverter design objectives that the transfer characteristic of an inverter is one of its key features. Consequently, understanding how to determine it for a given inverter and how to then design a particular inverter to achieve a desirable transfer characteristic are important.

In general, the transfer characteristic can be determined by summing the currents into the node at the top of the driver. The current from the voltage source through the load device and the current out the output terminal into the following gate(s) are typically functions of $v_{\text {OUT }}$ alone, whereas the current through the driver is a function of $v_{\mathrm{IN}}$ and possibly $v_{\mathrm{OUT}}$. Kirchhoff's current law applied to this node thus yields the desired relationship between $v_{\mathrm{IN}}$ and $v_{\text {OUT }}$.

If we have analytical expressions for terminal characteristics of the driver and load devices, we can determine the transfer characteristic analytically. We will see numerous examples of this in the following sections. Alternatively, it is often convenient and/or instructive to determine the transfer characteristic graphically. To do this, we can plot a family of curves relating the driver current to vout, with $\mathcal{v}_{\mathrm{IN}}$ as the stepped variable. On the same graph, the difference between the load current and the current into the following stage is plotted on the same axes; this curve is called the load line. The intersection of the load line and the driver


FIGURE 15.7
(a) Graphical determination of the static transfer characteristic of the inverter illustrated in (b). The actual transfer characteristic can be found in Fig. 15.11.
curve at a given $V_{\text {IN }}$ yields the corresponding $V_{\text {OUT }}$. This procedure is illustrated in Fig. 15.7 for an inverter we will study in Sec. 15.2.3.

### 15.2 MOSFET LOGIC

The MOSFET has proven to be the device par excellence for integrated circuit logic because of its relative simplicity (compared to bipolar transistors), small size, and low power demands (in large part because of its infinite input resistance); only in the area of speed does MOSFET logic circuitry fall short of bipolar logic circuitry. In this section we will look at several MOSFET logic families. They are all basically common-source circuits and differ only in the nature of their load devices.

The examples we will use to illustrate the different MOSFET logic families will all use $n$-channel enhancement mode MOSFETs as driver devices because they are faster than $p$-channel devices. Historically, however, the first commercial MOSFET logic used p-channel MOSFETs because it is more difficult to fabricate enhancement mode $n$-channel MOSFETs than enhancement mode $p$ channel devices. The problem lies in a naturally occurring positive-surface state charge density at the $\mathrm{Si}-\mathrm{SiO}_{2}$ interface (see Sec .9 .5 , page 257). Before it was learned how to control, minimize, and, ultimately, counterbalance the effects of this charge, $n$-channel devices tended to be solely depletion mode devices. We need not be overly concerned with these problems, of course, since they were solved before most of us were born, but they are nonetheless worth keeping in mind because they help explain the role that the various logic families we will
audy pared in the cooluton of the currently dominant technologies. We will thus mak referace th his hato at seved point in ile following sections.

### 15.2.1 Resistor Load

The simplest NOSFET incetter is an enhancement mode driver with a resistor Iow. as is illusmated in Fig. 15.8 . To andole this cercuit. we first write the
 whombip is impartant of because of the roles it plays, first in the swithing trantont and. second. in the transfer charateristic. We will discuss the swithing monion a bit later: for now we focus on the transer chatactenstic. In this inverter we mave

$$
\begin{equation*}
i_{l}=\frac{V_{n}-\operatorname{Hn}_{n} T}{R_{t}} \tag{15.8}
\end{equation*}
$$

 dathe this expresion for the had current to that for the driser drain current and tw whe the rexatang equation for row in tems of ros. The expreston tor the dran dran current depend on the state of the MOSFET driver, which in tum fepend on the relatise magmudes of the imput and output soltages, fin and ra, That is if in. which is identically $r$ is , is leos than $V_{7}$, the driver is off






$$
\begin{align*}
& i_{0}=0 \quad(15.9 \mathrm{a} \\
& \text { - vont lon }
\end{align*}
$$

$$
\begin{align*}
& \therefore r_{0}=V_{m}-\frac{R_{1} K}{2}\left(r_{n}-W_{7}\right)^{2} \tag{15.10a}
\end{align*}
$$

These characteristics are plotted in Fig. $15.8 b$ for a representative set of parameters: $V_{D D}=5 \mathrm{~V}, V_{T}=1 \mathrm{~V}$, and $R_{L} K=2 \mathrm{~V}^{-1}$. These values give a reasonable transfer characteristic with $V_{\text {LO }}$ approximately 0.6 V [obtained from solving Eq. (15.11b) with $V_{\mathrm{IN}}=V_{D D}$, i.e., $V_{\mathrm{HI}}$ ] and $V_{\mathrm{HI}}$ equal to 5 V [from Eq. (15.9b)]. It is highly desirable that $V_{L O}$ be less than $V_{T}$ so that the driver device is cut off when the input is low. The circuit designer, in general, has to choose $R_{L}$ and $K$ to achieve this result. We will not concern ourselves further with refining the design of this type of inverter stage because resistor loads are of little commercial interest. Instead, we will turn our attention to alternate loads.

Before leaving the resistor load, however, there are several additional points we should make. First, note that the on-to-off switching transient is simply an exponential with a time constant $R_{L} C_{L}$, assuming that the dynamic load is a linear capacitor of value $C_{L}$. That is, we have

$$
i_{L}=C_{L} \frac{d v_{\mathrm{OUT}}}{d t}=\frac{\left(V_{D D}-v_{\mathrm{OUT}}\right)}{R_{L}}
$$

Assuming that the inverter switches at $t=0$ and that $v_{\text {OUT }}=\nu_{\text {LO }}$ for $t \leq 0$, we find that $v_{\text {OUT }}$ is given as

$$
\begin{equation*}
v_{\text {OUT }}=V_{D D}-\left(V_{D D}-v_{\mathrm{LO}}\right) e^{-t / R_{L} C_{L}} \quad \text { for } t \geq 0 \tag{15.12}
\end{equation*}
$$

We will use this result as a point of reference when we discuss other loads below and when we discuss switching transients in detail in Chap. 16.

Second, notice that since $i_{D}$ is zero when the inverter is in its "off" state, $P_{\text {OFF }}$ is also zero. This is the primary motivation for insisting that $V_{\text {LO }}$ be less than the threshold voltage of the driver device.

And finally, because all of the stages we will look at in this section use the same type of switch (or driver) device, they share the same fan-in and fan-out features; it is thus appropriate to discuss these features now before proceeding to look at the other possible loads. First, the input to each stage is a MOSFET gate, so there is no static loading of the output of the preceding stages. The limit on fan-out will thus be determined by dynamic considerations, the topic of Chap. 16. Second, to obtain multiple inputs, we add driver devices in series as shown in Fig. $15.4 a$ for NAND operations or in parallel as in Fig. 15.4c for NOR operations.* As we have seen, an important design parameter is the driver $K$-factor, and when we have multiple driver devices we want to size them so that taken together they yield the target $K$-value. When the drivers (say there are $n$ of them) are in a series, this means we want to have the sum of the gate lengths, $n L$, divided by the gate width $W$ (which we assume is the same for all of the $n$ drivers) be equal to the target $W / L$ ratio. Since we usually design devices with the minimum gate length we can fabricate, this means that each input device should have a

[^25]gate width of $n W$ (i.e., $n W / n L=W / L$ ). When the drivers are in parallel, the situation is more complicated because having any combination of drivers on will switch the state of the inverter and it is impossible to have the same effective $K$-factor for all possible inputs. That is, if only one input is high, the effective driver gate width is $W$; if two are high it is $2 W$, etc. Fortunately, the performance of a MOSFET inverter stage in general improves as the $K$-factor of the driver is increased, so if in our design we assume one high input, things will only improve with more high inputs. Thus with multiple parallel drivers, we design them each to have the target $W / L$ ratio.

### 15.2.2 Enhancement Mode Loads

A major problem with using a resistor as a load is that the required resistors occupy a large area. In the above example, for instance, the $R_{L} K$ product was $2 \mathrm{~V}^{-1}$, and if we assume a typical $K$ value of 50 to $100 \mu \mathrm{~A} / \mathrm{V}^{2}$, we find a resistor value of 20 to $40 \mathrm{k} \Omega$ ! Such large values are achievable from thin resistive films deposited and patterned on the Si wafer surface, but rather than develop such a technology, most manufacturers have looked instead at using another MOSFET as a load. The MOSFETs that are most readily available for this purpose are enhancement mode MOSFETs like those used for the driver. They will have the same threshold but can have different $K$ values since changing $K$ involves only changing the $W / L$ ratio.

We will study two ways to use an enhancement mode load: with the gate and drain connected so that the load MOSFET is saturated, and with the gate tied to a separate supply so that the load MOSFET is always in its linear regime. We consider each in turn below.
a) Saturated load. The simplest way to use an enhancement mode MOSFET as a load is to connect its gate and drain as illustrated in Fig. 15.9a. Connected in this way, $v_{D S}$ is always greater than $\left(v_{G S}-V_{T}\right)$ for the load MOSFET, so it is always either saturated or cut off. Thus the load current in terms of $v_{\text {OUT }}$ is $K_{L}\left(V_{D D}-v_{\text {OUT }}-V_{T}\right)^{2} / 2$, where $K_{L}$ refers to the load device, as long as $v_{\text {OUT }}$ is less than ( $V_{D D}-V_{T}$ ); $i_{L}$ is 0 otherwise.

Once again the correct expression for the drain current of the driver device depends on the relative sizes of $v_{\mathrm{IN}}$ and $v_{\text {OUT }}$, and again we have three regions:

$$
\begin{array}{cl}
\text { Region I: } & \left(v_{\mathrm{IN}}-V_{T}\right) \leq 0 \quad\left[Q_{D} \text { cut off }\right] \\
& i_{D}=0 \\
& \therefore v_{\mathrm{OUT}}=V_{D D}-V_{T} \\
\text { Region II: } \quad & 0 \leq\left(v_{\mathrm{IN}}-V_{T}\right) \leq v_{\mathrm{OUT}} \quad\left[Q_{D} \text { saturated }\right] \\
& i_{D}=\frac{K_{L}}{2}\left(V_{D D}-v_{\mathrm{OUT}}-V_{T}\right)^{2}=\frac{K_{D}}{2}\left(v_{\mathrm{IN}}-V_{T}\right)^{2} \\
& \therefore v_{\mathrm{OUT}}=V_{D D}-V_{T}-\sqrt{\frac{K_{D}}{K_{L}}}\left(v_{\mathrm{IN}}-V_{T}\right) \tag{15.14b}
\end{array}
$$



FIGURE 15.9
(a) MOSFET inverter stage with an $n$-channel enhancement mode driver and a saturated $n$-channel enhancement mode load; (b) the static transfer characteristic, assuming $V_{D D}=6 \mathrm{~V}, V_{T}=1 \mathrm{~V}, K_{D}=50 \mu \mathrm{~A} / \mathrm{V}^{2}$, and $K_{L}=10 \mu \mathrm{~A} / \mathrm{V}^{2} ;(c)$ the current characteristic of the load.

$$
\begin{array}{ll}
\text { Region III: } & 0 \leq v_{\mathrm{OUT}} \leq\left(v_{\mathrm{IN}}-V_{T}\right) \quad\left[Q_{D} \text { linear }\right] \\
& i_{D}=\frac{K_{L}}{2}\left(V_{D D}-v_{\mathrm{OUT}}-V_{T}\right)^{2}=K_{D}\left(v_{\mathrm{IN}}-V_{T}-\frac{v_{\mathrm{OUT}}}{2}\right) v_{\mathrm{OUT}} \tag{15.15a}
\end{array}
$$

$$
\begin{equation*}
\therefore v_{\text {OUT }}: \text { quadratic function of } v_{\mathrm{IN}} ; \text { concave up } \tag{15.15b}
\end{equation*}
$$

This static transfer characteristic is plotted in Fig. $15.9 b$ assuming $V_{D D}=6 \mathrm{~V}$, $V_{T}=1 \mathrm{~V}, K_{L}=10 \mu \mathrm{~A} / \mathrm{V}^{2}$, and $K_{D}=50 \mu \mathrm{~A} / \mathrm{V}^{2}$. With these parameters $\nu_{\mathrm{HI}}$ is the same as in our resistor load example (i.e., 5 V ), so both inverters have to
charge their dynamic loads to comparable levels during the on-to-off transient. Also, $i_{L}$ is the same in both circuits when $v_{\mathrm{OUT}}=0$, which ensures that $P_{\mathrm{ON}}$ will be similar in both.

With these two considerations [i.e., comparable values of $\nu_{\mathrm{HI}}$ and $i_{L}(0)$ ], we can make meaningful comparisons between the performances of these two inverters. In particular, by comparing the two load current expressions that we have plotted in Figs. $15.8 c$ and $15.9 c$, respectively, we can immediately see that this circuit will switch through the on-off cycle much more slowly than will the inverter with the resistor load. The current through the saturated enhancement mode MOSFET load clearly falls below that through the resistor load, and thus $d v_{\text {Out }} / d t$ will be smaller. The problem is that the effective resistance of the load is too large; to make it smaller we have to turn on the load MOSFET more strongly, and to do so requires applying more bias to the gate. We will see how to do this next.
b) Linear load. The "fix" for the problem of the high effective resistance of the saturated load is to apply a bias $V_{G G}$ to the gate of the load MOSFET, as illustrated in Fig. 15.10a. The load current is now

$$
\begin{equation*}
i_{L}=K_{L}\left[V_{G G}-V_{T}-\frac{\left(V_{D D}-v_{\mathrm{OUT}}\right)}{2}\right]\left(V_{D D}-v_{\mathrm{OUT}}\right) \tag{15.16a}
\end{equation*}
$$

which in the limit of very large $V_{G G}$ approaches

$$
\begin{equation*}
i_{L} \approx K_{L}\left(V_{G G}-V_{T}\right)\left(V_{D D}-v_{\text {OUT }}\right) \tag{15.16b}
\end{equation*}
$$

Comparing this last expression to Eq. (15.7), you can see that they have identical forms and that the heavily biased MOSFET load looks like a linear resistor.

The transfer characteristic of this inverter circuit with $V_{D D}=5 \mathrm{~V}, V_{G G}=$ $15 \mathrm{~V}, V_{T}=1 \mathrm{~V}, K_{D}=50 \mu \mathrm{~A} / \mathrm{V}^{2}$, and $K_{L}=2 \mu \mathrm{~A} / \mathrm{V}^{2}$ is shown in Fig. 15.10b; the load current is plotted versus $v_{\text {OUT }}$ in Fig. 15.10c.

As a practical matter, adding a second voltage source $V_{G G}$ to the circuit is a bothersome complication, but not, as you might first guess, because it consumes significant additional power. This source actually supplies very little power because it is tied only to MOSFET gates and thus provides no quiescent current. The problem with adding $V_{G G}$ is that it must be wired to every logic gate in the circuit, which makes the entire integrated circuit larger than it would be otherwise and complicates the layout. Nonetheless, these circuits were used for a number of years, using p-channel MOSFETs, before the technology was developed to make $n$-channel MOSFETs and the inverter stages we will discuss next.

### 15.2.3 Depletion Mode Load: $n$-MOS

When we use an enhancement mode load we have to apply a large gate bias to get a switching speed that approaches that of a comparable inverter with a resistor load, but what we would really like to do is to switch even faster. To do this we need a load through which the current does not decrease as the output


## FIGURE 15.10

(a) MOSFET inverter stage with an $n$-channel enhancement mode driver and a linear $n$-channel enhancement mode load; (b) the static transfer characteristic assuming $V_{D D}=5 \mathrm{~V}, V_{G G}=15 \mathrm{~V}$, $V_{T}=1 \mathrm{~V}, K_{D}=50 \mu \mathrm{~A} / \mathrm{V}^{2}$, and $K_{L}=2 \mu \mathrm{~A} / \mathrm{V}^{2} ;(c)$ the current characteristic of the load.
voltage $v_{\text {OUT }}$ increases until $v_{\text {OUT }}$ has reached $v_{\mathrm{HI}}$. A device that approximates this behavior is a depletion mode MOSFET with $\nu_{G S}=0$; an inverter using such a MOSFET as a load is shown in Fig. 15.11a. For this circuit the load current $i_{L}$ is $K_{L} V_{T L}^{2} / 2$ when $v_{\text {OUT }}$ is less than ( $V_{D D}+V_{T L}$ ), where $V_{T L}$ is the threshold of the load device. (Note that $V_{T L}$ is negative for a depletion mode $n$-channel MOSFET.) When $v_{\text {OUT }}$ is greater than ( $V_{D D}+V_{T L}$ ), the load current $i_{L}$ is $K_{L}\left[-V_{T L}-\left(V_{D D}-v_{O U T}\right) / 2\right]\left(V_{D D}-v_{O U T}\right)$.

The transfer characteristic of this inverter is more complicated because both the load and driver devices can have several different states. It turns out that there are four regions of the characteristic:
Region I: $\quad\left(v_{\mathrm{IN}}-V_{T D}\right) \leq 0 \quad$ [ $Q_{D}$ cut off, $Q_{L}$ linear]

$$
\begin{equation*}
i_{D}=0 \tag{15.17a}
\end{equation*}
$$

$$
\begin{equation*}
v_{\text {OUT }}=V_{D D} \tag{15.17b}
\end{equation*}
$$

Region II: $\left.0 \leq\left(\nu_{\mathrm{IN}}-V_{T D}\right) \leq\left(V_{D D}\right)+V_{T L}\right) \leq \nu_{\text {OUT }} \quad$ [ $Q_{D}$ saturated, $Q_{L}$ linear]

$$
\begin{equation*}
i_{D}=K_{L}\left[-V_{T L}-\frac{\left(V_{D D}-v_{\mathrm{OUT}}\right)}{2}\right]\left(V_{D D}-v_{\mathrm{OUT}}\right)=\frac{K_{D}}{2}\left(v_{\mathrm{IN}}-V_{T D}\right)^{2} \tag{15.18a}
\end{equation*}
$$

$v_{\text {OUT }}$ : quadratic function of $v_{\text {IN }}$; concave down
Region III: $0 \leq\left(v_{\text {IN }}-V_{T D}\right) \leq v_{\text {OUT }} \leq+\left(V_{D D}+V_{T L}\right) \quad\left[Q_{D}\right.$ and $Q_{L}$ saturated]
$i_{D}=\frac{K_{L}}{2} V_{T L}^{2}=\frac{K_{D}}{2}\left(v_{I N}-V_{T D}\right)^{2}$.
$v_{\text {OUT }}:$ any value from $\sqrt{\frac{K_{L}}{K_{D}}}\left|V_{T L}\right|$ to $\left(V_{D D}+V_{T L}\right)$
$v_{\mathrm{IN}}=V_{T D}+\sqrt{\frac{K_{L}}{K_{D}}}\left|V_{T L}\right|$
Region IV: $0 \leq v_{\text {OUT }} \leq\left(v_{\text {IN }}-V_{T D}\right) \quad\left[Q_{D}\right.$ near, $Q_{L}$ saturated]
$i_{D}=\frac{K_{L}}{2} V_{T L}^{2}=K_{D}\left(v_{\mathrm{IN}}-V_{T D}-\frac{v_{\mathrm{OUT}}}{2}\right) v_{\mathrm{OUT}}$
$\nu_{\text {OUT }}$ : quadratic function of $\nu_{\mathbb{N}}$; concave up
This transfer characteristic is plotted in Fig. $15.11 b$ (solid curve) using $V_{D D}=5 \mathrm{~V}$, $V_{T D}=1 \mathrm{~V}, V_{T L}=-1 \mathrm{~V}, K_{D}=50 \mu \mathrm{~A} / \mathrm{V}^{2}$, and $K_{L}=250 \mu \mathrm{~A} / \mathrm{V}^{2}$. Correspondingly, $V_{\mathrm{HI}}$ is $5 \mathrm{~V}, V_{\mathrm{LO}}$ is approximately 0.7 V , and $V_{\mathrm{TR}}$ is approximately 3.2 V . Notice from Eq. (15.19c) that the input voltage at which the curve is vertical in region III (which is also the value of $V_{\mathrm{TR}}$ ) is determined by the threshold voltages and the ratio of $K_{L}$ to $K_{D}$. We can use this dependence to optimize the noise margins in this logic family.

Region III in this characteristic deserves a bit more discussion. It is vertical according to our simple large-signal model, but in reality it has a finite slant due


FIGURE 15.11
(a) MOSFET inverter stage with an $n$-channel enhancement mode driver and an $n$-channel depletion mode load; (b) the static transfer characteristic assuming $V_{D D}=5 \mathrm{~V}, V_{T D}=1 \mathrm{~V}$, $V_{T L}=-1 \mathrm{~V}, K_{D}=50 \mu \mathrm{~A} / \mathrm{V}^{2}$, and $K_{L}=250 \mu \mathrm{~A} / \mathrm{V}^{2}$; (c) the current characteristic of the load; ( $d$ and $e$ ) graphical illustration of the construction of the transfer characteristic in the vicinity of the steepest portion for $v_{B S L}=0$ and $v_{B S L} \neq 0\left(=v_{\text {OUT }}\right)$, respectively.
to the finite output conductances of the two MOSFETs and the substrate effect on the load MOSFET. This is perhaps easiest to see graphically. In the simple model we assume that the output characteristics of both the load and driver devices are flat in saturation, as shown in Fig. 15.11d. If this is indeed the case, there will be a value of $v_{\text {IN }}$ for which the load line and driver characteristic overlap over a considerable range of $v_{\text {OUT }}$. The effect of a nonzero output conductance, however, is to put a slight slope in these characteristics, as shown in Fig. 15.11e, so they can still intersect but can never overlap. In the case of the load device, the changing substrate bias as $v_{\text {OUT }}$ varies leads to an appreciable slope in the load line, as is indicated by the dotted load lines in Figs. 15.11c and $e$. Rather than being vertical, then, the output characteristic will have a finite slope in region III, as shown by the dotted curve labeled $v_{B S L} \neq 0$ in Fig. 15.11b. Thus the dotted lines in Figs. $15.17 b$ and $c$ show the effects of accounting for the nonzero substrate bias $v_{B S}$ ( $=v_{\text {OUT }}$ ) on the load.

We can evaluate this slope using our small-signal models; in fact, we have done so already in Sec. 11.4.1b, although we didn't think in such terms there. In Chap. 11, we consider the incremental gain of this same circuit biased at points in regions II and III of this transfer characteristic. Referring back to that discussion we see that the incremental gain, which is the slope, in region III is $-g_{m D} /\left(g_{o L}+g_{o D}+g_{m b L}\right)$, or approximately $-g_{m D} / g_{m b L}$ since $g_{o L}$ and $g_{o D}$ should be very small. This in turn can be written as $-K_{D}^{1 / 2} / \eta K_{L}^{1 / 2}$, and in this form we can estimate it. We have $\left(K_{D} / K_{L}\right)^{1 / 2}$ roughly 0.4 in the example of Fig. $15.11 b$, so if we assume $\eta$ is, for example, 0.1 , we find a slope of 4 . This is a lot less than infinity, and we clearly have to refine our large-signal model to account for the dependence of $V_{T}$ on $v_{B S}$ if we want to do more accurate modeling of this inverter stage. There is no need to do so for our present purposes, but it is important that you be aware that our simple model has limitations. You should in general be suspicious of any model when it predicts something is either zero or infinity. Another equally important lesson from this discussion is that the incremental and large-signal models must be consistent and must yield the same results. It is OK for one model to predict something the other does not if the relevant effect was included in the former and not in the latter, but you want to recognize and understand that if the predictions differ and you cannot identify the reason, then something is wrong.

In terms of the depletion mode load, implementing this configuration in an integrated circuit requires that we be able to make two types of MOSFETs on the same chip. Since the problem with early $n$-channel MOSFETs was that their threshold was hard to control and tended to be negative (i.e., they were depletion mode), the development of this logic family went hand-in-hand with the development of $n$-channel MOSFETs. The problems were solved in large part through the use of polycrystalline silicon gates (see Fig. 10.10b) and the use of ion implantation to control the threshold voltages by adjusting the effective interface charge density $Q_{S S}$. There was already a big incentive to use $n$-channel rather than $p$-channel MOSFETs since the electron mobility is significantly higher than the hole mobility. This means that, all else being equal, $n$-channel devices have
higher gain and are intrinsically faster. Thus since ion implantation was required to make $n$-channel logic work, there was little technological cost in implanting some devices to make their thresholds positive and leaving the others with negative thresholds. Since previous technologies had used p-channel MOSFETs, this "new" $n$-channel, depletion-mode-load, silicon-gate MOSFET logic technology was called simply $n$-MOS, for short.

The big win in $n$-MOS then is improved speed for comparable power, both because $n$-channel MOSFETs are used and because the load current stays high until $v_{\text {OUT }}$ is very near $V_{\mathrm{HI}}\left(=V_{D D}\right)$, as shown in Fig. 15.I1c. Therefore $d v_{\text {OUT }} / d t$ stays large over most of the on-to-off transient. With this load we have at last done better than we could with a simple, albeit large, resistor. In the next subsection we see how we can do even better.

### 15.2.4 Complementary Load: CMOS

A way to improve on the depletion mode load in terms of speed and power, which are the performance factors we tend to focus on since they are the ones that differ from load to load, is to increase the load current above its "on" value $I_{\text {ON }}$ during the on-to-off switching transient. This sounds a bit tricky to do at first, but it turns out to be very easy if you use a $p$-channel enhancement mode MOSFET as the load and connect its gate to that of the driver and thus also to $\nu_{\mathrm{IN}}$, as illustrated in Fig. 15.12a. Now when $\nu_{\text {IN }}$ is $\nu_{\mathrm{HI}}$ and what we have been calling the driver is "on," the load MOSFET is off, so $I_{\mathrm{ON}}$ is zero. Thus $P_{\mathrm{ON}}$ is zero, and since $P_{\text {OFF }}$ is also zero, power is dissipated in this inverter only during switching.

During the on-off switching cycle the driver is turned off, but the load is turned on and its load characteristic looks exactly like that of the depletion mode load. By sizing the devices so that $K_{L}=K_{D}$ and $V_{T L}=-V_{T D}$, the two switching transients, on-to-off and off-to-on, can be made equally fast. It becomes a bit academic to distinguish between the driver and the load devices in such a symmetric situation.

The static transfer characteristic now has five regions; deriving it is thus tedious but still very straightforward. For completeness we will enumerate this multitude of regions here, but your attention is called especially to regions III and V (we will discuss these two regions somewhat later below):

$$
\begin{array}{ll}
\text { Region I: } & \left(v_{\mathrm{IN}}-V_{T N}\right) \leq 0 \leq v_{\text {OUT }} \quad\left[Q_{n} \text { cut off }\right] \\
& \left(v_{\mathrm{IN}}-V_{D D}-V_{T P}\right) \leq\left(v_{\text {OUT }}-V_{D D}\right) \leq 0 \quad\left[Q_{p} \text { linear }\right] \\
& i_{D}=0 \\
& v_{\text {OUT }}=V_{D D} \\
\text { Region II: } & 0 \leq\left(v_{\mathrm{IN}}-V_{T N}\right) \leq v_{\text {OUT }} \quad\left[Q_{n} \text { saturated }\right] \\
& \left(v_{\mathrm{IN}}-V_{D D}-V_{T P}\right) \leq\left(v_{\text {OUT }}-V_{D D}\right) \leq 0 \quad\left[Q_{p} \text { linear }\right] \\
& i_{D}=\frac{K_{N}}{2}\left(v_{\mathrm{IN}}-V_{T N}\right)^{2} \tag{15.22a}
\end{array}
$$



FIGURE 15.12
(a) MOSFET inverter stage with an $n$-channel enhancement mode driver and a $p$-channel enhancement mode load (this inverter with its complementary pair of MOSFETs is called CMOS); (b) the static transfer characteristic assuming $V_{D D}=5 \mathrm{~V}, V_{T N}=1 \mathrm{~V}, V_{T P}=-1 \mathrm{~V}$, and $K_{N}=K_{P}=50 \mu \mathrm{~A} / \mathrm{V}^{2}$. (c) the current supplied to the following stage through $Q_{P}$ as a function of $v_{\text {OUT }}$ for two values of $v_{\text {IN }}$.

$$
\begin{equation*}
=K_{P}\left[v_{\mathrm{IN}}-v_{D D}-V_{T P}-\frac{\left(v_{\mathrm{OUT}}-V_{D D}\right)}{2}\right]\left(v_{\mathrm{OUT}}-V_{D D}\right) \tag{15.22b}
\end{equation*}
$$

$v_{\text {OUT }}$ : quadratic function of $v_{\text {IN }}$; concave down
Region III: $0 \leq\left(v_{\mathrm{IN}}-V_{T N}\right) \leq v_{\text {OUT }} \quad\left[Q_{n}\right.$ saturated]

$$
\begin{align*}
& \left(v_{\text {OUT }}-V_{D D}\right) \leq\left(v_{\mathrm{IN}}-V_{D D}-V_{T P}\right) \leq 0 \quad\left[Q_{P} \text { saturated }\right] \\
& i_{D}=\frac{K_{N}}{2}\left(v_{\mathrm{IN}}-V_{T N}\right)^{2}=\frac{K_{P}}{2}\left(v_{\mathrm{IN}}-V_{D D}-V_{T P}\right)^{2}  \tag{15.23a}\\
& v_{\mathrm{IN}}=\frac{\sqrt{K_{P}}\left(V_{D D}+V_{T P}\right)+\sqrt{K_{N}} V_{T N}}{\sqrt{K_{P}}+\sqrt{K_{N}}} \tag{15.23b}
\end{align*}
$$

$\left(=V_{D D} / 2\right.$ if $V_{T P}=-V_{T N}$ and $\left.K_{p}=K_{N}\right)$
$v_{\text {OUT }}$ : any value between ( $\nu_{\text {IN }}-V_{T N}$ ) and ( $\nu_{\text {IN }}-V_{T P}$ ) (15.23c)
Region IV: $0 \leq \nu_{\text {OUT }}\left(\nu_{\text {IN }}-V_{T N}\right)$ [ $Q_{n}$ linear]

$$
\begin{align*}
& \left(v_{\mathrm{OUT}}-V_{D D}\right) \leq\left(v_{\mathrm{IN}}-V_{D D}-V_{T P}\right) \leq 0 \quad\left[Q_{P} \text { saturated }\right] \\
& i_{D}=K_{N}\left(v_{\mathrm{IN}}-V_{T N}-\frac{v_{\mathrm{OUT}}}{2}\right) v_{\mathrm{OUT}}=\frac{K_{P}}{2}\left(v_{\mathrm{IN}}-V_{D D}-V_{T P}\right)^{2} \tag{15.24a}
\end{align*}
$$

$v_{\text {OUT }}$ : quadratic function of $v_{\mathrm{IN}}$; concave up
Region V: $0 \leq v_{\text {OUT }} \leq\left(v_{I N}-V_{T N}\right) \quad$ [ $Q_{n}$ linear]

$$
\begin{align*}
& \left(v_{\text {OUT }}-V_{D D}\right) \leq 0 \leq\left(v_{\mathrm{IN}}-V_{D D}-V_{T P}\right) \\
& i_{D}=0  \tag{15.25a}\\
& v_{\text {OUT }}=0 \tag{15.25b}
\end{align*}
$$

The transfer characteristic is illustrated in Fig. $15.12 b$ for a CMOS gate for which $V_{D D}=5 \mathrm{~V}, V_{T N}=1 \mathrm{~V}, V_{T P}=-1 \mathrm{~V}$, and $K_{N}=K_{P}=50 \mu \mathrm{~A} / \mathrm{V}^{2}$. For this gate $V_{L O}$ is $0 \mathrm{~V}, V_{\mathrm{HI}}$ is $5 \mathrm{~V}, V_{T R}$ is 2.5 V , and the curve is very steep, characteristics you will recognize (based on our discussion in Sec. 15.1.3) as extremely attractive for a good noise margin. Notice, however, that achieving such a symmetrical transfer characteristic requires that we have $K_{N}$ and $K_{P}$ equal and that the threshold voltages have the same magnitude.

Region $V$ is of interest because there, as well as in region I, one of the MOSFETs is cut off, so $V_{\text {Lo }}$ goes all the way to zero just as $V_{\mathrm{HI}}$ increases to $V_{D D}$. That is, the voltage swings through the entire available range.

Region III is of interest because the simple large models predict that it will be vertical. As was the case with the depletion mode load, however, we know that it isn't truly vertical because of the finite output conductance of any real MOSFETs. (There is no substrate effect in this inverter because we can short both substrates to the respective source.) Doing a small-signal analysis of this inverter for a bias point in region III yields a voltage gain of $-2 g_{m} /\left(g_{o N}+g_{o P}\right)$. This is also the slope of the transfer characteristic in this region, and although it is not
infinite, it clearly is indeed very large, unlike what we found to be true for the depletion mode load inverter. The secret is being able to keep the substrate bias $\nu_{B S}$ from changing with $\nu_{\text {OUT }}$; in this family it is zero on both devices.

To make multiple-input gates in this inverter family we have to add both driver and load devices. To make an $n$-input NOR gate, for example, we put $n n$-channel MOSFETs in parallel, as in Fig. $15.4 d$, and $n$ p-channel MOSFETs in series. To make NAND gates the $n$-MOSFETs are in series and the $p$-MOSFETs in parallel. In all cases the gates of the $n$-and $p$-channel devices are connected in pairs for each input.

This inverter family is called CMOS, for complementary-MOS; the term complementary comes from the use of both $n$ - and $p$-channel enhancement mode devices. Simultaneously producing both $n$ - and $p$-channel MOSFETs on the same silicon substrate (an example is pictured in Fig. 11.17 and the process is discussed in Appendix G) requires much more additional processing but is well worth the effort in many situations. The main reason is that the static power is zero in CMOS and power is dissipated only during switching. Referring to Eq. (15.6), we find that for CMOS we have

$$
\begin{equation*}
P_{\mathrm{ave}}=f_{\mathrm{CLOCK}} E_{\mathrm{CYCLE}}=f_{\mathrm{CLOCK}} C_{L} V_{D D}^{2} \tag{15.26}
\end{equation*}
$$

where to obtain the last expression we have assumed that the charge store on the output node can be modeled as an ideal linear capacitor $C_{L}$. The powerdelay product is thus simply $C_{L} V_{D D}^{2}$, a result that shows clearly the advantage of reducing the power supply voltage.

CMOS is, like $n$-MOS, a potentially very fast technology; both have been used in very fast MOS logic circuits. At the same time, however, the fact that the static power dissipation in CMOS circuits is negligible has led to their application in many relatively slow circuits. Many devices that do not require blinding speed, such as simple pocket calculators and wristwatches, use CMOS for its low power requirements.

### 15.3 BIPOLAR INVERTERS

The bipolar junction transistor is distinctly different from the MOSFET, and these differences have led, as we shall see, to different solutions to the challenges of inverter design. On the one hand, BJTs operate at higher current levels than MOSFETs, which has made it possible to design bipolar inverter families that operate at speeds well beyond what has been achieved with MOSFETs. At the same time, however, BJTs do not have an infinite input resistance like a MOSFET, and their operation can involve large charge stores. These "problems" tend to complicate BJT inverter design and lead to relatively more complex inverter circuits than those used with MOSFETs. Consequently bipolar logic tends to be applied where high speed is essential and worth the cost in complexity and power that must be paid to use BJTs. It is also being used increasingly in combination with MOSFETs, using one of a number of BiMOS processes designed to integrate MOS and bipolar devices on the same integrated-circuit chip. In these circuits each device
can be used where it functions best: the MOSFETs for the bulk of the computation and memory, and the bipolar to provide the high currents necessary to interface with the off-chip world.

In the following subsections we will take a first look at bipolar transistor inverter designs. We begin with a simple bipolar inverter built around resistors and a single transistor switch. After analyzing this circuit and considering its limitations, we study its evolution into higher-performance transistor-transistor logic, TTL. Finally, we look briefly at still more advanced bipolar logic families.

### 15.3.1 The Simple Bipolar Inverter

The simplest bipolar inverter you might imagine is a single BJT used as a switch and a resistor load like the circuit illustrated in Fig. 15.13a. This circuit is analogous to the MOSFET inverter with a resistor load pictured in Fig. 15.8. A little thought about this circuit, however, shows that it will draw an excessive amount of current from the stage preceding it. That is, there is very little to limit the current when the input is high. This loading clearly also affects the "high" voltage level, limiting it to on the order of 0.6 V . Although logic operations could be performed using such an inverter, the voltage swings and noise margins are very low and get worse with increasing fan-out. Furthermore, the power requirements are excessive, and the circuit is simply not attractive. We immediately see that the low input resistance of a BJT necessitates a more complicated response.

To limit the input current a simple "fix" is to add a resistor in series with the base, as illustrated in Fig. 15.13b. This circuit now is much less power-


FIGURE 15.13
Simple bipolar inverters: (a) a single BJT used as a switch with a resistor load; $(b)$ the same circuit with a resistor added to the base circuit to limit the loading on the preceding stage and to increase the output voltage swing. (The latter circuit is the basic building block for resistor-transistor logic, RTL.)
hungry and has reasonable high and low voltage levels. To calculate the transfer characteristic we need to take into account the loading from the succeeding stage since it does draw current through the load, unlike the situation in a MOSFET inverter. Thus we want to calculate $\nu_{\text {OUT }}$ versus $\nu_{\text {IN }}$ for the circuit as modeled in Fig. 15.14a, where we have used the simplified piecewise-linear breakpoint model instead of the full Ebers-Moll model. Notice that we have assumed that the output is fanning out to $n$ similar stages, so the effective resistance seen at the output is $R_{B} / n$.

The breakpoints of the various diodes in Fig. 15.14a define regions in the transfer characteristics, and we can write expressions relating $v_{\text {OUT }}$ and $\nu_{\text {IN }}$ in each. For example, when $\nu_{\text {IN }}$ is less than 0.6 V the transistor is off and $\nu_{\text {OUT }}$ is constant and equal to $\left[0.6+\left(V_{C C}-0.6\right) R_{B} /\left(R_{B}+n R_{C}\right)\right]$. For $v_{\mathrm{IN}}$ greater than $0.6 \mathrm{~V}, i_{B}$ is $\left(v_{\mathrm{IN}}-0.6\right) / R_{B}$. The value of $v_{\text {OUT }}$ will then be given by $\left[R_{B} V_{C C}+0.6 R_{C}\left(\beta_{F}+n\right)-\beta_{F} R_{C} v_{\mathrm{IN}}\right] /\left(R_{B}+n R_{C}\right)$, so long as it is greater than 0.6 V . When $v_{\text {OUT }}$ drops below 0.6 V the transistors in the following stages turn off and $v_{\text {OUT }}$ becomes $\left[V_{C C}-\beta_{F}\left(v_{\mathrm{IN}}-0.6\right) R_{C} / R_{B}\right.$ ] and continues to drop until it reaches 0.2 V , at which point it remains constant at this value. In this region, of course, the transistor is in saturation. These transfer characteristics are plotted in Fig. $15.14 b$ for an inverter for which $V_{C C}=5 \mathrm{~V}, R_{B}=10 \mathrm{k} \Omega, R_{C}=1 \mathrm{k} \Omega$, and $\beta_{F}=50$, and for fan-outs of 1 and 4 .

This simple resistor-transistor logic (RTL) inverter stage has limitations that led designers to look for alternatives. First, it uses large-value resistors, which


FIGURE 15.14
(a) Resistor-transistor logic circuit of Fig. $15.13 b$ modeled using the breakpoint diode approximation to the Ebers-Moll model; $(b)$ the static transfer characteristic calculated with this model and $V_{D D}=5 \mathrm{~V}, R_{B}=10 \mathrm{k} \Omega, R_{C}=1 \mathrm{k} \Omega$, and $\beta_{F}=50$ (characteristics are shown for fan-outs of 1 and 4).
are always a concern with integrated circuits. Second, it is sensitive to fan-out and fan-in of the following stages (though we didn't look at fan-in here).* Finally, this circuit is slowed by the fact that the transistor gets driven into saturation. To switch the transistor off, this excess charge must be removed through $R_{B}$, and the $R C$ time constant associated with this path can be large. One solution to this problem has been to replace the current-limiting resistors in the base (i.e., the $R_{B}$ resistors) with other elements, in particular diodes and transistors. We shall consider this course of action next.

### 15.3.2 Transistor-Transistor Logic: TTL

The main problem with the very simple bipolar inverter pictured in Fig. 15.13a is that it draws a large current from the preceding stage and pins the output voltage at a low value. Adding a base resistor solves these problems but is not a totally satisfactory solution, as we have just seen. Another approach is to supply the current from the main power supply and within the stage itself, and then to use the input to send it into the base when $\gamma_{\mathrm{IN}}$ is high or shunt it to ground when $\nu_{\mathrm{IN}}$ is low. The concept is illustrated in Fig. 15.15a. A problem with this idea, however, is that it still pins the input at a very low upper bound (i.e., approximately 0.6 V ) since the input is still not buffered from the base of the switch transistor.

A way to provide the needed buffering is to use a diode at the input, as illustrated in Fig. 15.15b. Now when the input is "high," the input diode is reverse-biased and there is no loading of the preceding stage. When the input is low, the current source is no longer shunted to ground but is held 0.6 V above ground by the forward drop of the input diode. This is not low enough to turn the transistor off, however, so a second diode must be added in series with the switch transistor base to ensure that the switch transistor is indeed not turned on.

In practice, we do not need to go to the complication of using a true current source in this stage, but can more easily use a resistor as shown in Fig. 15.15c. This inverter forms the basis for what is called diode-transistor logic, (DTL) and was widely used for discrete component logic.

The problem with the DTL inverter in Fig. $15.15 c$ appears when we try to turn off the switching transistor, bringing it out of saturation and into cutoff. To do this, the excess charge in the base and collector regions of the device has to be removed, and in this circuit this charge cannot be pulled out of the base because the diode connected to the base node blocks current flow out of the base. The solution is to replace the back-to-back diodes pictured in Fig. $15.15 c$ with an $n p n$ transistor as shown in Fig. $15.15 d$. When the input is high the circuit behaves pretty much as it did before. It now does load the preceding stages a little bit

[^26]
(a)

(c)

(b)

(d)

## FIGURE 15.15

(a) Simple bipolar inverter with an integral current source to reduce the input loading but with inadequate isolation or buffering at the input to achieve a large voltage level swing; (b) the circuit of (a) modified by adding diodes to isolate the input terminal from the base-emitter junction and thereby achieve the sought-after reduced loading and to allow for a larger input voltage swing; (c) the circuit of (b) with the current source replaced by a resistor; (d) the circuit of (c) with a transistor replacing the back-to-back diodes.
because the transistor $Q_{B}$ is in its reverse active region and $\beta_{R}$ is not zero, but this is a small effect. The real change occurs during the switching cycle when $v_{\mathrm{IN}}$ suddenly becomes low. $Q_{B}$ is then operating in its forward active region and actually draws current out of the base of $Q_{D}$; this results in a much shorter on-off switching time.

The inverter concept pictured in Fig. $15.15 d$ is the basis for transistortransistor logic (TTL). Numerous refinements and tweaks in this basic structure have been developed over the years, and there are actually many flavors of TTL optimized for particular applications: low-power/low-speed, high-power/high-speed, etc. We will focus our attention on the two-input TTL gate illustrated in Fig. 15.16a.

To help you understand this circuit a similar DTL gate is shown in Fig. 15.16b. Looking first at the DTL circuit and comparing it to the DTL inverter in Fig. $15.15 c$, we see that an additional diode has been added in series with the base terminal of $Q_{D}$ to increase the noise margin for a low input; that is, now $Q_{D}$ will not begin to turn on until the input exceeds 1.2 V rather than 0.6 V .

Returning to the TTL gate in Fig. $15.16 a$ we see that the added diode in Fig. $15.16 b$ becomes another transistor $Q_{D}$ in a Darlington connection with $Q_{S}$ in the TTL gate. This additional transistor helps buffer the input and increases the noise margin. It does block $Q_{B}$ from pulling the stored charge out of the base of $Q_{S}$ ( $Q_{B}$ now pulls charge out of $Q_{D}$ ), but the resistor $R_{E}$ can be small enough that $Q_{S}$ can discharge quickly through it to ground during the on-off switching cycle.

Another new feature of this TTL gate is the use of the transistor $Q_{L}$ in the output circuit. This output combination, $Q_{L}$ and $Q_{S}$, is called a "totem-pole" connection; it functions similarly to a push-pull output stage (see Sec. 13.2.5) and is analogous to the use of a depletion mode load in $n$-MOS or a $p$-channel load in CMOS. When the output switches from low to high, the current needed to charge up the output node (i.e., mainly the input capacitances of the following stages) is supplied through $Q_{L}$, rather than $R_{C}$ as before. $Q_{L}$ supplies a larger, constant current, much like the depletion mode in the $n$-MOS, for example, and this reduces the on-off switching time. When the output switches from high to low, the load is discharged through $Q_{S}$.

Finally, note that the circuit in Fig. $15.16 a$ is a two-input gate rather than a simple inverter. What is interesting is that multiple inputs are achieved by adding emitters to $Q_{B}$. Pulling any one emitter low turns $Q_{B}$ on and results in a high output; thus logically this is a NAND gate. Structurally adding another emitter involves simply enlarging the area of the base region and placing the added emitter within it. It involves no additional processing.

Another thing we can do without additional processing is to add diodes to the circuit that keep the transistors in the gate from going into saturation. This change has a major impact on the switching speeds because it eliminates the largest charge stores. To prevent saturation we do what is called clamping: very simply, a diode with a low turn-on voltage and small diffusion capacitance is placed in parallel


FIGURE 15.16
(a) Two-input TTL NAND/AND gate with a second stage of input buffering and a totem-pole output stage; (b) similar DTL stage to indicate the role of the additional diode drop at the input in increasing the turn-on and trigger voltages.
with the base-collector junction. When that junction is reverse-biased, as it is in the forward active region or cutoff, the reverse-biased clamping diode has no impact on the operation of the gate. When the base-collector junction is forwardbiased, however, the clamping diode turns on and diverts the current away from the transistor junction. Very little, if any, flows across the base-collector junction, and there is no excess charge stored in the transistor. If the clamping diode has much less excess charge storage at a given current level than would the transistor, we gain a large speed advantage.

Fortunately it is very easy to make a diode that meets the two criteria we have set for the clamping diode (i.e., low turn-on voltage and small charge storage) simply by making metal contact on the lightly doped collector region. Recall from our discussion of contacts to $n$ - and $p$-type silicon in Sec. 6.4 that we said it was necessary to heavily dope the $n$-region next to the contact in order to get a good ohmic contact. If we do not do this, we get a contact with a nonlinear currentvoltage characteristic, and if the $n$-region is lightly doped, as it is in the typical collector, the characteristic is actually that of a very good diode. Furthermore this diode has a relatively low turn-on voltage, and when it is forward-biased all of the current flow is comprised of carriers flowing from the semiconductor to the metal (i.e., there is negligible minority carrier injection into the semiconductor). Such a diode, called a Schottky diode, is an ideal clamp and is easily implemented. The concept of a Schottky clamp and its realization are illustrated in Fig. E. 6 in Appendix E. (Appendix E discusses metal-semiconductor diodes in detail; you do not need to read it in order to understand the Schottky clamp and Fig. E.6, but you may find it interesting.)

With the introduction of the Schottky clamp and TTL circuits that do not saturate, it has even been feasible in some designs to return to diode-transistor logic for some portions of more complex gates. As you should recall, our main argument for TTL over DTL was that in DTL we could not pull charge out of the base of the saturated switch transistor. With the need to do so eliminated, this drawback of DTL disappears as well.

### 15.3.3 Emitter-Coupled Logic: ECL

Another very successful way to use bipolar transistors for binary logic is to build upon the transfer characteristic of the emitter-coupled pair. This characteristic, which we calculated in Sec. 12.2.1 and displayed in Fig. 12.4, certainly has the right shape and is in fact very sharp, being only a few $k T / q$ wide. More significantly, it turns out to be possible, as we shall see, to design logic inverters based on the emitter-coupled pair in which the transistors do not saturate and thus are very fast. Furthermore, we can obtain both an output and its inverse from the same gate. This logic type is called emitter-coupled logic, or ECL.

An illustrative ECL inverter is shown in Fig. 15.17. The input is applied to one of the transistors, $Q_{1}$, of the emitter-coupled pair, and a reference voltage $V_{\text {REF }}$ is applied to the base of the other, $Q_{2} . V_{\text {REF }}$ is typically chosen to be midway between $V_{\text {LO }}$ and $V_{H I}$; that is,

$$
\begin{equation*}
V_{\mathrm{REF}}=\frac{\left(V_{\mathrm{HI}}+V_{\mathrm{LO}}\right)}{2} \tag{15.27}
\end{equation*}
$$

The output is taken via an emitter-follower, $Q_{3}$, from either the collector of $Q_{1}$ if the inverted output is desired or $Q_{2}$ if the noninverted output is sought.

To understand the operation and design of this inverter, consider first applying $V_{\text {LO }}$ to the input, in which case $Q_{1}$ is to be off and $Q_{2}$ should be on.


FIGURE 15.17
(a) Basic emitter-coupled logic inverter (the circuitry supplying the reference voltage $V_{\mathrm{REF}}$ to the base of $Q_{2}$ is not shown); (b) the transfer characteristics of this inverter for values of $V_{C C}$ of 3 and 5 V and a logic swing of 0.8 V .

Assuming that this is indeed the case, we see that node 1 is at $V_{C C}$ and that $v_{\text {OUT }}$ is $V_{C C}-0.6 \mathrm{~V}$. This output voltage must be $V_{\mathrm{HI}}$, so we have

$$
\begin{equation*}
V_{\mathrm{HI}}=V_{C C}-0.6 \tag{15.28}
\end{equation*}
$$

We can also find an expression for the voltage on node 2 , which must be $V_{\mathrm{LO}}+0.6 \mathrm{~V}$. The current through $R_{3}$, which we label $i_{3}$, is $\left(V_{\mathrm{REF}}-0.6\right) / R_{3}$, so the voltage on node 2 is also $V_{C C}-R_{2}\left(V_{\text {REF }}-0.6\right) / R_{3}$. Equating these two expressions gives us an expression for the ratio $R_{2} / R_{3}$, that is,

$$
\begin{equation*}
\frac{R_{2}}{R_{3}}=\frac{\left(V_{C C}-V_{\text {LO }}-0.6\right)}{\left(V_{\text {REF }}-0.6\right)} \tag{15.29a}
\end{equation*}
$$

which, using Eqs. (15.27) and (15.28), can also be written as

$$
\begin{equation*}
\frac{R_{2}}{R_{3}}=\frac{2\left(V_{\mathrm{HI}}-V_{\mathrm{LO}}\right)}{\left(V_{\mathrm{HI}}+V_{\mathrm{LO}}-1.2\right)} \tag{15.29b}
\end{equation*}
$$

Next consider applying $V_{\mathrm{HI}}$ to the input, which should turn $Q_{1}$ on and $Q_{2}$ off. With $Q_{1}$ on, the voltage on node 1 should be $V_{L O}+0.6$. We can also write the voltage on this node as $V_{C C}-R_{1} i_{3}$, where $i_{3}$ is not $\left(V_{\mathrm{HI}}-0.6\right) / R_{3}$. Combining these expressions we find that

$$
\begin{equation*}
V_{\mathrm{LO}}+0.6=V_{C C}-\frac{R_{1}}{R_{3}}\left(V_{\mathrm{HI}}-0.6\right) \tag{15.30a}
\end{equation*}
$$

Using Eq. (15.28) and rearranging terms, this becomes

$$
\begin{equation*}
\frac{R_{1}}{R_{3}}=\frac{\left(V_{\mathrm{HI}}-V_{\mathrm{LO}}\right)}{\left(V_{\mathrm{HI}}-0.6\right)} \tag{15.30b}
\end{equation*}
$$

To complete our compilation of design equations, we finally note that bounds are placed on the voltage swing ( $V_{\mathrm{HI}}-V_{\mathrm{LO}}$ ). For example, we do not want $Q_{1}$ to be saturated when $\nu_{\mathrm{IN}}$ is $V_{\mathrm{HI}}$ and $Q_{1}$ is on, so we must have the voltage on node 1 , which is then $V_{\mathrm{LO}}+0.6 \mathrm{~V}$, no less than $V_{\mathrm{HI}}-0.4 \mathrm{~V}$. Thus we must have

$$
\begin{equation*}
V_{\mathrm{HI}}-\left(V_{\mathrm{LO}}+0.6\right) \leq 0.4 \tag{15.31a}
\end{equation*}
$$

which tells us that

$$
\begin{equation*}
\left(V_{\mathrm{HI}}-V_{\mathrm{LO}}\right) \leq 1.0 \tag{15.31b}
\end{equation*}
$$

Similarly, we assume that $Q_{1}$ is off when $v_{\mathrm{IN}}$ is $V_{\mathrm{LO}}$ and that $Q_{2}$ is off when $v_{\mathrm{IN}}$ is $V_{\mathrm{HI}}$. If we assume that $Q_{1}$ and $Q_{2}$ will be off when their emitter-base voltages are less than 0.4 V , we find that $V_{\text {REF }}$ must fall within the following bounds:

$$
\begin{equation*}
V_{\mathrm{LO}}+0.2 \leq V_{\mathrm{REF}} \leq V_{\mathrm{HI}}-0.2 \tag{15.32}
\end{equation*}
$$

Combining this result with Eq. (15.27) gives us a lower bound on the voltage swing, namely

$$
\begin{equation*}
\left(V_{\mathrm{HI}}-V_{\mathrm{LO}}\right) \leq 0.4 \tag{15.33}
\end{equation*}
$$

Combining this result with Eq. (15.31b), we find that ( $V_{\mathrm{HI}}-V_{\mathrm{LO}}$ ) is bounded as follows:

$$
\begin{equation*}
0.4 \leq\left(V_{\mathrm{HI}}-V_{\mathrm{LO}}\right) \leq 1.0 \tag{15.34}
\end{equation*}
$$

It makes sense to choose the swing to be on the high side, and a typical value is 0.8 V . Once we make this choice and decide on the value of the supply voltage $V_{C C}$, we can use Eqs. (15.28) through (15.30) to calculate the resistor values and determine the voltages.

## Example

Question. Suppose that we have $V_{C C}=5 \mathrm{~V}$ and $V_{\mathrm{HI}}-V_{\mathrm{LO}}=0.8 \mathrm{~V}$. What will $V_{\mathrm{HI}}, V_{\mathrm{LO}}$, and $V_{\mathrm{REF}}$ be, and what values should $R_{1}, R_{2}$, and $R_{3}$ have? How do these values change if $V_{C C}=3 \mathrm{~V}$ ?

Discussion. Calculating the voltages, we find $V_{\text {LO }}=3.6 \mathrm{~V}, V_{\mathrm{HI}}=4.4 \mathrm{~V}$, and $V_{\mathrm{REF}}=4.0 \mathrm{~V}$. From Eqs. (15.29b) and (15.30b), for the resistor ratios we find that $R_{1} / R_{3}=0.21$ and $R_{2} / R_{3}=0.235$. Thus if $R_{3}$ is $1 \mathrm{k} \Omega$, for example, $R_{1}$ must be $210 \Omega$, and $R_{2}$ must be $235 \Omega$.

With $V_{C C}=3 \mathrm{~V}$, we find $V_{\mathrm{LO}}=1.6 \mathrm{~V}, V_{\mathrm{HI}}=2.4 \mathrm{~V}$, and $V_{\mathrm{REF}}=2.0 \mathrm{~V}$. The resistor ratios are now $R_{1} / R_{3}=0.445$ and $R_{2} / R_{3}=0.57$. With $R_{3}=1 \mathrm{k} \Omega$, we find $R_{1}=445 \Omega$ and $R_{2}=570 \Omega$. We thus see that we can still design an inverter that gives the same magnitude of voltage swing with a lower voltage supply; this is important because it will reduce the power dissipation significantly.

The transfer characteristics of the ECL gate we have just analyzed for the conditions corresponding to the above example are plotted in Fig. 15.17b. Plots
for supply voltages $V_{C C}$, of both 3 and 5 V are presented. In making these sketches (and they are just that-sketches) it was assumed that the emitter-base diodes start to conduct at a forward bias of 0.4 V and are completely on at a forward voltage of $0: 6 \mathrm{~V}$. The voltage swing in ECL is considerably smaller than it has been for the other logic gates we have investigated, but the transfer characteristic is also sharper. For this reason, and because this is largely a current-controlled gate, the noise stability of ECL is actually very good in spite of its relatively small voltage noise margins.

To create a multiple-input ECL gate, we can place additional input transistors in parallel with $Q_{1}$, in the spirit of Fig. 15.4d. Since we can get both the inverted and noninverted outputs from a single stage, such a gate can simultaneously provide both the NOR and OR of the inputs. To achieve the NAND and AND functions in ECL we have to duplicate the entire emitter-coupled pair for each input and connect their outputs together at the input to $Q_{3}$, which then in effect performs the logic operation.

In an actual ECL gate, $V_{\mathrm{REF}}$ will be obtained from the main voltage supply $V_{C C}$ through a resistive voltage divider and buffer transistor. A single such reference circuit may be used to supply a $V_{\text {REF }}$ signal to several gates on a single chip or in an integrated circuit. Typically, a $-5.2-\mathrm{V}$ supply is used to power ECL gates. Using a negative supply simply means that the terminal marked $V_{C C}$ in Fig. 15.17 is actually grounded; the grounded terminal in this figure is connected to the negative supply.

Because it realizes nonsaturating bipolar logic in a relatively simple and extremely fast circuit configuration, ECL has become the dominant bipolar logic family. It has been realized in compound semiconductors such as gallium arsenide, as well as in silicon, and is the benchmark against which competing high-speed technologies are measured.

### 15.4 MEMORY CELLS

The memory cell is the basic building block for a semiconductor memory in much the same way that an inverter is the basic building block for semiconductor logic. Memory cells can themselves also be built up from inverters, as we shall see below, but because they are such a specialized and important element, many memory cell designs have been developed and optimized for their own sake, often largely independently of inverter designs (independently, that is, except for issues relating to the problems of interfacing between logic and memory). In the following two subsections we will first look at memory cells that derive directly from inverter concepts and represent what is called static, but volatile, memory. We will also look briefly at cells that qualify as nonvolatile static memory cells. Finally, we will look at dynamic memory cells; these cells do not derive directly from inverter designs but are, of course, fabricated on the same chip with inverterbased logic circuitry and thus are fabricated simultaneously with the inverters and using the same process technology.

In general, any memory cell is designed to be used in a two-dimensional array of cells arranged in rows and columns. Thus, in addition to how a cell stores information, an equally important part of any cell design is the way in which that cell is selected from or identified in the array for purposes of either writing information (i.e., a 1 or a 0 ) into it or reading information out of it. The objective is to have a design in which a signal applied to one row of the array and another signal applied to one column of the array will access the cell at the intersection of the chosen row and column and will not affect any other cell in the array. We shall see examples of how this is done as we look at specific cells shortly.

Because memory cells are employed in large arrays, two obvious objectives in their design are (1) making them as small as possible and (2) reducing the power dissipation in each cell to a minimum. We will want to keep these objectives in mind as we look at different approaches to memory in the following subsections.

### 15.4.1 Static Memory Cells

By static memory we mean a memory that retains its information indefinitely, but by indefinitely we don't mean forever; we distinguish between two types of static memory: volatile and nonvolatile. Volatile memory loses its information if the power supply is removed; the information in a sense evaporates. Nonvolatile memory does not lose its information when it is unpowered. We will discuss examples of each in turn.
a) Volatile static memory cells. The ring connection of two inverters in Fig. 15.1 c constitutes a memory cell called a flip-flop. Such a ring, or flip-flop, has two states: the first inverter on and the second off, or the first inverter off and the second on. The flip-flop will stay in whichever condition it is placed indefinitely, which is why we can call it static, unless the power supply is removed, which is why it is also volatile.

An example of an $n$-MOS flip-flop is shown in Fig. 15.18a, and an entire $n$-MOS static memory cell including the addressing MOSFETs is shown in Fig. 15.18b. The operation of the basic flip-flop should be obvious to you based on our discussions in Sec. 15.2.3. The flip-flop is addressed and accessed through additional enhancement mode MOSFETs used in essentially a common-gate mode to either sense, or "read," the state of the flip-flop or to actually change the state of the flip-flop, if necessary, when writing information into the memory cell.

The row-select line is normally maintained at a voltage below the enhancement mode MOSFET threshold $V_{T e}$, so $Q_{5}$ and $Q_{6}$ are not on when the appropriate row-select line is not activated. To access a row, the row-select line voltage is raised to $V_{D D}$, turning $Q_{5}$ and $Q_{6}$ on. The column read/write select lines, when not activated, are maintained at a standby voltage $V_{\text {REST }}$, intermediate between $V_{\mathrm{HI}}$ and $V_{\mathrm{LO}} . V_{\mathrm{REST}}$ is selected, and $Q_{5}$ and $Q_{6}$ are sized so that their conductance is small enough that turning them on in this condition does not affect the state of the flip-flop. Thus if, for example, $Q_{1}$ is on and $Q_{2}$ is off, closing $Q_{5}$ must not


FIGURE 15.18
(a) $n$-MOS flip-flop; (b) an $n$-MOS static memory cell built around a flip-flop and including row and column read and write access circuitry.
cause node 1 to rise above $V_{T e}$ and closing $Q_{6}$ must not cause node 2 to drop below $V_{T e}$. The latter will not occur because node 2 will clearly fall somewhere between $V_{\text {REST }}$ and $V_{D D}$ (both of which will be greater than $V_{T e}$ ) assuming that $Q_{2}$ stays off, but node 1 can rise above $V_{T e}$ if too much current flows into this node through $Q_{5}$. For this reason, the $K$-factor of $Q_{5}$ (and $Q_{6}$ ) must be smaller than that of $Q_{1}$ and $Q_{2}$, and $V_{\text {REST }}$ cannot be too high. (We will find additional constraints on these quantities below.)

To read the state of a particular cell in the selected row, the appropriate column lines are disconnected from $V_{\text {REST }}$ and are allowed to assume the voltages of the corresponding nodes 1 and 2 of the cell. By sensing the voltage difference between the two lines, we can determine whether node 1 or 2 is higher, and thus whether a zero or a one is stored in the cell.

To write data into the flip-flop, one of the column lines is lowered to ground while the other is maintained at $V_{\text {REST }}$. For the sake of discussion, suppose the column line connected to $Q_{5}$ is grounded. The intent is that this will force node 1 below $V_{T e}$, turning $Q_{2}$ off, which in turn will turn $Q_{1}$ on. When the column line is returned to $V_{\mathrm{REST}}$, the flip-flop remains in the selected state. For this sequence to work, however, the conductance of $Q_{5}$ must be sufficient that the voltage on node 1 drops below $V_{T e}$; this requirement places another restriction on the $K$-factor of $Q_{5}$ (and $Q_{6}$ ) and on $V_{\text {REST }}$. We will not go through the mathematics required to determine a self-consistent set of $K$-factors and value for $V_{\mathrm{REST}}$, but doing so involves only a straightforward, albeit tedious, application of our large-signal MOSFET model and considerable algebra.
b) Nonvolatile static memory cells. It has not proven practical to date to produce nonvolatile memory cells into which data can be written rapidly. That is, it has not been possible to find a method of storing information in a semiconductor memory cell in which the state can be changed easily and quickly if so desired and that will also retain its state information if power is lost (i.e., a cell that is nonvolatile). The best that has been achieved with nonvolatile cells is to create cells whose state can be changed relatively slowly and with considerable effort, so they are best used in situations where they are for the most part only read and seldom if ever written (i.e., changed). It turns out, however, that there is a considerable demand for such read-mostly memory cells, and even for read-only memory cells (i.e., cells that are never changed and are only read). Furthermore, such read-only cells can be extremely simple and very small, so they can be built into relatively large arrays.

(a)


FIGURE 15.19
Static, nonvolatile read-only and read-mostly memory cells: (a) the basic memory cell concept; (b) its implementation in MOS technology; (c) its implementation in bipolar technology. In (b) and (c) the device on the left represents storage of a 0 , the one on the right storage of a 1 .

Nonvolatile memory cells tend to all be based on a relatively simple concept: A transistor switch is placed where each column and row line cross. It is connected in such a fashion that if the row is activated the switch either closes or remains open, depending on whether there is a 0 or 1 at that location, thereby either connecting the column line to ground or leaving it isolated from ground. This idea is illustrated in Fig. 15.19a.

The easiest way to ensure that a given switch will not close when a row line is activated is not to form the connection between the control electrode and the row line, as illustrated on the left side of Figs. $15.19 b$ and $15.19 c$, for MOSFET and bipolar versions, respectively, of such a read-only memory (ROM) cell. Clearly, the information in this type of memory cell must be written in at the time of manufacture.

With MOSFETs it has proven to be possible in some structures to alter the threshold electrically or optically. These devices can be used to make memories of this type that can be changed, albeit not easily, and that thus are suitable for read-mostly memories, or RMMs. The idea is that connection is made to every gate in an array like that shown in Fig. 15.19b, but the threshold voltage of some of the devices is changed so that the voltage applied to the row line is not sufficient to turn them on. The low-threshold devices do turn on and connect the corresponding column lines to ground, but the high-threshold devices do not.

There are several techniques that have been successfully used to implement this type of read-mostly memory. Most involve changing the threshold by somehow placing charge either directly in the gate dielectric or on another electrode placed between the gate electrode and the channel. Doing this typically involves applying a very large voltage to the device and momentarily breaking down the dielectric so that the charge moves through it and into the desired position. To erase the memory (i.e., to set all of the cells back to zero), the cells can be illuminated with high-energy ultraviolet light. This light is sufficient to generate hole-electron pairs in the gate insulator, turning it temporarily into a conductor (this is in fact photoconductivity, just like we studied in Sec. 3.3), allowing the stored charge to leak off. There are also memory cell technologies of this type in which the stored charge can be removed by applying a sufficiently high erase bias to the cell.

### 15.4.2 Dynamic Memory Cells

At the other extreme of the spectrum from static memory cells are cells that lose their state even if power is continuously applied. At first it might seem that this is not a very useful type of memory cell, but it turns out that these cells can be made so compact and fast that they are practical to use, even if they must be repeatedly read and rewritten (we call it "refreshed") so that the information stored in them is not lost. The space gained by being able to make the cells much smaller is considerably more than that which is lost because of the peripheral circuitry needed to refresh the cells. Furthermore, since the cells are much smaller, the rows and columns can be much shorter, making access faster. Alternatively, a memory can have more rows and columns (i.e., can store more information) before it becomes too large.


FIGURE 15.20
Dynamic random-access memory cells: (a) the circuit schematic of a single transistor cell; (b) a possible implementation shown in cross section; (c) the schematic of a three-transistor cell (the additional transistors in this latter cell provide amplification of the stored charge, making it easier to sense the state of the cell.)

The simplest dynamic memory cell consists of a single transistor (usually a MOSFET) and a capacitor, as pictured in Fig. 15.20a. An integrated implementation of this cell is shown in cross section in Fig. 15.20b. The idea is that a 1 is written into the cell by raising the appropriate row and column lines high, turning the transistor on and charging up the capacitor. When the lines are returned to their low state, the capacitor remains charged. To read a cell, the appropriate row line is raised, again turning the transistor on, and the presence or absence of charge on the capacitor is determined by sensing whether or not charge has flowed onto the appropriate column line.

There are clearly some problems with this scheme that have to be addressed. First, there is the matter of how the charge is stored. The capacitor, however it is formed, is connected to the drain $n^{+}$-region of the MOSFET, and thus there is a reverse-biased $p-n$ junction diode between the capacitor and ground. Consequently, the capacitor will eventually discharge to ground through this diode. We
can very simply estimate the time it will take for this to occur as follows: Assume that the capacitor value is $C$, that it is charged up to $V_{D D}$ at time zero, and that the diode saturation current is $I_{S}$. The diode current will be essentially constant at $-I_{S}$; this current is $C d v / d t$, so the stored charge will clearly decay linearly with time as

$$
\begin{equation*}
Q(t)=C V_{D D}-I_{S} t \quad \text { for } t<\frac{C V_{D D}}{I_{S}} \tag{15.35}
\end{equation*}
$$

and it will be zero in $C V_{D D} / I_{S}$ seconds. Typically we say that $Q(t)$ can decay to 50 percent of its maximum value before we can no longer tell whether the cell was originally charged or not. This then sets the maximum refresh cycle period.

A second problem with this cell is that the state of the cell is effectively reset to zero every time it is read (see the next paragraph for more discussion of this), so the data must be rewritten every time the cell is read. This requires additional peripheral circuitry and increases the memory access time.

A final problem with this cell design is that when the state of the cell is read, the charge originally on the storage capacitor is distributed between this capacitor and the capacitance of the column lines and the circuitry attached to it. If this represents a large capacitive load, as it typically does, the corresponding voltage change may be very small and difficult to detect, even if $C$ is fully charged. The solution to this problem is to amplify the charge by adding more transistors, and thereby gain, to the cell. A three-transistor cell that implements this idea is shown in Fig. $15.20 c$. This design does not eliminate the problem of the cell's volatility and the need to regularly refresh it, but because the cell has gain, less charge can be sensed and the refresh period can be made considerably longer. It is still necessary, however, to rewrite the cell after reading it.

The one- and three-transistor dynamic memory cells we have just seen are widely used to realize fast random-access memories (RAMs) on digital integrated circuits because of their simplicity, small size, and speed. They are very important elements in modern system design.

### 15.5 SUMMARY

In this chapter we have studied basic building-block circuits for binary logic and memory. For logic, the basic building block is the inverter. We have shown that an important feature of any inverter is its transfer characteristic, and we have identified several key parameters of inverters that provide criteria for comparing and optimizing inverter designs, including the high and low voltage levels, the switching speed, the fan-in and fan-out capability, the power dissipation, and the noise margins. We have studied MOS and bipolar versions of inverters. As a general rule, we have found that MOS inverters can be relatively simple because of the high input resistance of the MOSFET. Bipolar inverters, for their part, tend to be larger and more complicated than MOS inverters, involve higher current levels, and dissipate more power, but they are also faster.

For memory, the basic building block is the memory cell. We have looked at static memory cells, both volatile and nonvolatile, and at dynamic memory cells. In our brief introduction, we have seen that MOS memory cells can be realized
with even a single transistor and can be used to realize large-scale, high-density random-access memory.

## PROBLEMS

15.1 Design an MOS logic circuit using depletion mode loads to have the truth table given in Table P15.1.

This function is called the majority logic function.
15.2 An important parameter in any MOSFET inverter design is the ratio of $K_{L}$ to $K_{D}$.
(a) Investigate the effect of varying this ratio on the transfer characteristics of the $n$-MOS inverter in Fig. 15.11 by sketching the characteristics for $K_{1}=$ $50,100,250$, and $500 \mu \mathrm{~A} / \mathrm{V}^{2}$. Use the other device parameters as given in the caption of the figure. In your sketch do accurate plots in regions I and III and sketches in regions II and IV. Ignore the body effect (i.e., assume $\eta=0$ ).
$\because$ (b) From your results in part a, suggest an optimum $K_{L} / K_{D}$ for the best noise margin.
15.3 Answer the questions posed in problem 15.2 for the CMOS inverter in Fig. 15.12 (i.e., assuming $K_{N}=50 \mu \mathrm{~A} / \mathrm{V}^{2}$ ) and for $K_{P}=50,100,250$, and $500 \mu \mathrm{~A} / \mathrm{V}^{2}$.
15.4 This question, and the following one, concern the design of the $K$-factors of the individual driver FETs in a multiple-input NOR gate.
(a) Draw the circuit schematic of a two-input $n$-MOS NOR gate.
(b) Sketch the transfer characteristic of this gate assuming one input is zero; that is, plot $v_{C}$ versus $v_{A}$ with $v_{B}=0$ (the notation refers to Fig. 15.4d). Assume $V_{D D}=5 \mathrm{~V}, V_{T D}=1 \mathrm{~V}, V_{T L}=-1 \mathrm{~V}, K_{D}=50 \mu \mathrm{~A} / \mathrm{V}^{2}$, and $K_{L}=$ $200 \mu \mathrm{~A} / \mathrm{V}^{2}$.
(c) Repeat part b with $v_{B}=\nu_{A}$. Do your sketch on the same set of axes you used in part b.
(d) Repeat parts b and c assuming $K_{D}=25 \mu \mathrm{~A} / \mathrm{V}^{2}$.
(e) From your results in parts b through d , suggest a strategy for sizing $K_{D}$ in multiple-input $n$-MOS NOR gates.
15.5 Answer the questions posed in problem 15.4 for multiple-input $n$-MOS NAND gates (refer to Fig. 15.4b).
15.6 You are assigned the task of laying out the gates of the driver devices in the $n$ MOS equivalent of the logic gates in Fig. 15.4, and you are told that you have the following constraints and design objectives:

Table P15.1

| INPUTS |  |  | OUTPUTS |  |
| :---: | :---: | :---: | :---: | :---: |
| $\boldsymbol{A}$ | $\boldsymbol{B}$ | $\boldsymbol{C}$ | $\boldsymbol{D}$ |  |
| 0 | 0 | 0 | 0 |  |
| 1 | 0 | 0 | 0 |  |
| 0 | 1 | 0 | 0 |  |
| 0 | 0 | 1 | 0 |  |
| 1 | 1 | 0 | 1 |  |
| 1 | 0 | 1 | 1 |  |
| 0 | 1 | 1 | 1 |  |
| 1 | 1 | 1 | 1 |  |

The minimum gate length $L$ is $1^{\prime} \mu \mathrm{m}$.
The minimum gate width $W$ is $2 \mu \mathrm{~m}$.
The effective driver $K$-factor $K_{D}$ is to be $50 \mu \mathrm{~A} / \mathrm{V}^{2}$ when all the driver devices in a given stage are on.
The $K$-factor of a minimum-geometry device (i.e., with $W=2 \mu \mathrm{~m}$ and $L=1 \mu \mathrm{~m}$ ) is $20 \mu \mathrm{~A} / \mathrm{V}^{2}$.
The total gate area is to be kept to a minimum.
(a) Specify the gate dimensions of $D_{1}, D_{2}$, and $D_{3}$ in the AND gate in Fig. 15.4b.
(b) Do the same for $D_{1}, D_{2}$, and $D_{3}$ in the OR gate in Fig. 15.4d.
(c) Do the same for $D_{1}, D_{2}, D_{3}$, and $D_{4}$ in the LOGIC gate in Fig. 15.4f.
15.7 The layout rules given in Fig. 15.4 for multiple-input gates don't quite work with CMOS since both the $n$-channel and $p$-channel MOSFETs in a CMOS inverter are turned on and off (i.e., act as switches and also as loads). Recognizing the complementary nature of the $n$ - and $p$-channel devices and the complementary nature of the NOR and NAND functions, draw the circuit schematic of the following CMOS gates.
(a) two-input NAND gate
(b) two-input NOR gate
(c) three-input gate having truth table in Fig. 15.4e.
15.8 With an eye toward reducing the power dissipation in his CMOS product line, your employer asks you to assess the impact on the static transfer characteristics and noise margins of reducing the power supply from 5 V to 3 V .
(a) Calculate and plot the transfer characteristic of the CMOS inverter in Fig. 15.12 when $V_{D D}=3 \mathrm{~V}$. Nothing else is changed.
(b) It should be clear to you from your result in part a that it will be desirable to reduce the magnitudes of the threshold voltages of the $n$ - and $p$-channel MOSFETs in these inverters. Recalculate the transfer characteristics assuming, first, that $V_{T N} \equiv\left|V_{T P}\right|=0.75 \mathrm{~V}$, and, then, that $V_{T N}=\left|V_{T P}\right|=0.5 \mathrm{~V}$.
(c) A logic gate requiring a $3-\mathrm{V}$ supply can be powered by three $1.1-\mathrm{V}$ batteries. However, once operation off three batteries is achieved, the logical next step is to try to use two and perhaps even one battery to do the job. Comment on the constraints that doing this places on the threshold voltages and on what happens to the noise margins.
15.9 In the circuit pictured in Fig. P15.9, the transistor $Q_{1}$ has $\beta=25$ and the EbersMoll model parameters, $I_{E S}$ and $I_{C S}$, are $10^{-13} \AA$ and $5 \times 10^{-12} \AA$, respectively. Frequently, the full Ebers-Moll model is not necessary and $v_{B E, \text { on }}=0.6 \mathrm{~V}$ and $v_{C E, \text { sat }}=0.2 \mathrm{~V}$ are adequate approximations.
(a) With the input open-circuited and no load attached to the output (i.e., with the output also open-circuited), what are the following quantities? You may assume $v_{B E, \text { on }}=0.6$ and should first confirm that $Q_{1}$ is biased in its forward active region.
(i) The collector current $I_{C}$
(ii) The output voltage $V_{O}$
(iii) The voltage at the input terminal $V_{I}$
(b) To answer this question assume $v_{B E \text {,on }}=0.6 \mathrm{~V}$ and $v_{C E, \text { sat }}=0.2 \mathrm{~V}$. Assume also that the output terminal remains open-circuited as in part a.
(i) When $v_{\mathrm{IN}}=0 \mathrm{~V}$, in which region is the transistor $Q_{1}$ biased (cutoff, forward active, or saturation) and why? What is $v_{\text {OUT }}$ in this situation (i.e., when $\left.\nu_{\mathrm{IN}}=0 \mathrm{~V}\right)$ ?


FIGURE P15.9
(ii) When $v_{\text {IN }}=6 \mathrm{~V}$, in which region is the transistor $Q_{1}$ biased (cutoff, forward active, or saturation) and why? What is $v_{\text {OUT }}$ in this situation?
15.10 Consider the circuit in Fig. P15.10a containing two identical transistors, $Q_{1}$ and $Q_{2}$. You may model these transistors using $\beta_{F}=50, v_{B E, O N}=0.6 \mathrm{~V}$, and $v_{C E, S A T}=$ 0.2 V .
(a) With $\nu_{\mathrm{IN}}=0 \mathrm{~V}, Q_{1}$ is cut off and $Q_{2}$ is saturated. What are $\nu_{\text {MID }}$ and $\nu_{\mathrm{OUT}}$ ?
(b) Estimate how large $v_{\text {IN }}$ can be before $v_{\text {MID }}$ and $v_{\text {OUT }}$ change from their values in part a.
(c) To reduce power dissipation, it is desirable to make $R_{B}$ as large as possible. What is the maximum value of $R_{B}$ that will keep $Q_{2}$ saturated when $Q_{1}$ is off?
(d) What is the total power dissipation in this circuit when $v_{\mathrm{IN}}=0$ so $Q_{1}$ is off and $Q_{2}$ is saturated? Use $R_{B}=15 \mathrm{k} \Omega$ and $R_{L}=5 \mathrm{k} \Omega$.
Now consider a similar circuit fabricated using two identical enhancement mode MOSFETs as shown in Fig. P15.10b.
(e) For what range of $v_{\mathrm{IN}}$ between 0 and 6 V will $Q_{1}$ be off?
$(f)$ When $Q_{1}$ is off, in which region is $Q_{2}$ biased and what is $v_{\text {OUT }}$ ?


FIGURE P15.10 $a$


FIGURE P15.10 $b$
15.11 The inverter chain pictured in Fig. P15.11 is made with silicon npn bipolar transistors having the following parameters: $N_{E}=10 N_{B}=100 N_{C} ; w_{E}=w_{B}=$ $0.2 w_{C}$; and $\beta=20$. The value of the current source is 0.1 mA .
(a) Sketch and dimension the transfer characteristic, $v_{\text {OUT }}$ versus $v_{\text {IN }}$, for one inverter stage.
(b) What are the "high" and "low" logic levels of this inverter?
15.12 Draw the circuit schematics for the following emitter-coupled logic (ECL) gates:
(a) two-input NOR
(b) two-input OR
(c) two-input NAND

Your NAND circuit should show you why designers avoid the NAND and AND functions when working with ECL.
15.13 The logic levels and transfer characteristic of an emitter-coupled logic gate depend only on the ratio of the resistor values in the circuit.
(a) Why is this a desirable situation?
(b) As an ECL designer, how do you choose the values of the resistors $R_{1}, R_{2}$, and $R_{3}$ in Fig. 15.17? That is, what is the optimal value for $R_{1}$ ? Be sure


FIGURE P15.11
to state what "optimal" means to you and why optimal is not equivalent to unique.
(c) On what basis would a designer select $R_{4}$ in Fig. 15.17 ? (Your answer to this question may be different before and after you read Chap. 16.)
(d) What is the power dissipation in each of the ECL gates designed in the example in Sec. 15.33 on page 533 , that is, in the $5-\mathrm{V}$ and $3-\mathrm{V}$ designs?

## CHAPTER 16

## SWITCHING TRANSIENTS IN DEVICES AND CIRCUITS

In this chapter we will address the question of how quickly devices and simple inverters can be switched from one steady-state condition to another and what design options we have available to make them switch faster. How quickly, for example, will a bipolar transistor turn on if we suddenly increase its base-emitter voltage from zero to a value in the forward active region? Or to a value in saturation? And what can be done with the device structure to minimize this turn-on delay? How quickly, for example, will the output of a CMOS NOR gate become high after one of its inputs has been changed from high to low? And what performance penalties do we suffer in terms of power, noise margin, or other factors when we redesign the gate to make it faster? How quickly can we read data into or out of a particular cell in a memory? And how does the access time scale with the size of the memory?

The issues in this chapter are the large-signal, time-domain equivalents for inverter building-block stages of the small-signal, sinusoidal steady-state issues we addressed for linear amplifier stages in Chap. 14.

When we speak of switching transients, as we do in the title of this chapter, we imply an interest in how the terminal voltages and currents evolve while the state of a device or circuit is changing, as well as an interest in knowing how long it takes the change to occur. Predicting the actual current and voltage waveforms during a switching transient is often difficult to do using hand calculations, however, because we are dealing with nonlinear devices and large signals. Detailed waveform analysis is usually best done by computer, and excellent transient
analysis programs are available for this purpose. Consequently, we focus our efforts here on developing an intuitive feel for the switching process and, for the most part, on simply estimating the duration of the transient.

We begin with the general problem of estimating the duration of switching transients in nonlinear circuits, and we will develop several simplified methods for doing so. Then we will look at the behavior of individual devices when we suddenly switch their inputs. Finally, we will look at using the insight we have gained on devices to analyze some representative digital circuits.

### 16.1 GENERAL TECHNIQUES

As we have seen earlier, there is stored charge associated with the operation of any electronic device, and it is this stored charge that determines the switching transient. That is, changing the state of a device or circuit involves changing the amount of charge stored in that device or circuit, and this takes time.

The time rate of change of the charge store associated with any circuit node is determined by the net current into that node. If we have a node $A$ with an associated charge store $q_{\mathrm{A}}$ and with $N$ currents $i_{\mathrm{A} n}$ flowing into it, then

$$
\begin{equation*}
\frac{d q_{\mathrm{A}}}{d t}=\sum_{n=1}^{N} i_{\mathrm{A} n} \equiv i_{\mathrm{A}} \tag{16.1}
\end{equation*}
$$

Notice that we have written the total net current into the node as $i_{\mathrm{A}}$.
Writing the charge $q_{\mathrm{A}}$ and the currents $i_{\mathrm{A} n}$ as functions of the node voltages in the circuit ( $v_{A}, v_{B}, v_{C}$, etc.) and doing this for each node (A, B, C, etc.) gives us a set of coupled differential equations that can be solved for the transient node voltage signals $\left[v_{\mathrm{A}}(t), v_{\mathrm{B}}(t), v_{\mathrm{C}}(t)\right.$, etc.] that we seek.

To see how this works in a familiar situation, consider a circuit containing an ideal linear capacitor. Both nodes, A and B, of a linear capacitor have charges associated with them that are linearly related to the size of the capacitor and the voltage difference between the two terminals. We write for an ideal linear capacitor $C$ that

$$
\begin{gather*}
q_{\mathrm{A}}=C v_{\mathrm{AB}}  \tag{16.2a}\\
q_{\mathrm{B}}=C v_{\mathrm{BA}}\left(=-q_{\mathrm{A}}\right) \tag{16.2b}
\end{gather*}
$$

Summing the currents into node $A$, for example, we have

$$
\begin{equation*}
i_{\mathrm{A}}=\sum_{n=1}^{N} i_{\mathrm{An}}=\frac{d q_{\mathrm{A}}}{d t}=C \frac{d v_{\mathrm{AB}}}{d t} \tag{16.3a}
\end{equation*}
$$

Now, to continue this exercise, assume that this capacitor is connected to a circuit that contains only linear resistors and sources (and no other capacitors). This circuit can therefore be represented by its Thevenin equivalent circuit, and we have $i_{\mathrm{A}}=\left(V_{S}-v_{\mathrm{AB}}\right) / R_{S}$, where $V_{S}$ and $R_{S}$ are the Thevenin equivalent voltage and resistance, respectively, of the circuit connected to the capacitor. Using this in Eq. (16.3a), we arrive at the familiar result

$$
\begin{equation*}
R_{S} C \frac{d v_{\mathrm{AB}}}{d t}=V_{S}-v_{\mathrm{AB}} \tag{16.3b}
\end{equation*}
$$

This relationship is linear, and we know all about solving linear differential equations. We also know how to solve problems like this involving circuits that contain several linear capacitors.

So far so good, but the charge stored in a nonlinear electronic device is typically a nonlinear function of the terminal voltages. Thus the stored charge associated with a node is in general not linearly related to the voltage on that terminal, and if the voltage changes, the change in the amount of stored charge is in general a complicated nonlinear function of the change in voltage. That is, unlike the situation in an ideal linear capacitor, we cannot write the change in the amount of stored charge as some constant $C$ times the change in voltage; that is

$$
\begin{equation*}
\left.\Delta q_{\mathrm{A}} \equiv q_{\mathrm{A}}\right|_{V_{A B}=V_{F}}-\left.q_{\mathrm{A}}\right|_{V_{\mathrm{AB}}=V_{I}} \neq C\left(V_{F}-V_{I}\right) \tag{16.4a}
\end{equation*}
$$

when $C$ is a constant independent of $v_{A B}$. In the above equation, $V_{F}$ represents the voltage after the change and $V_{I}$ is the voltage before. Often it is convenient to write the above expression more compactly as

$$
\begin{equation*}
\Delta q_{\mathrm{A}} \neq C \Delta v_{\mathrm{AB}} \tag{16.4b}
\end{equation*}
$$

We have seen earlier in nonlinear problems that for small-signal variations about a quiescent bias point, it is useful to define a capacitance $C$ that is a function of the quiescent voltage $V_{\mathrm{AB}}$,

$$
\begin{equation*}
\left.C\left(V_{\mathrm{AB}}\right) \equiv \frac{d q_{\mathrm{A}}}{d v_{\mathrm{AB}}}\right|_{\nu_{\mathrm{AB}}=V_{\mathrm{AB}}} \tag{16.5}
\end{equation*}
$$

but for large-signal variations, which we are currently discussing, this is not useful. We must deal with the nonlinearity in a different way.

To address this new problem we will begin by making two assumptions. First, we assume that we are more interested in the duration of a switching transient than in its detailed shape. Second, we assume that the transient is dominated by the charging of only one element and thus that we need only be concerned with the charging of one node. Label this node as A, and proceed as follows: From quiescent (dc) analyses we determine the initial and final voltages on node $A$. Then we calculate the corresponding initial and final charge stores and from their difference calculate the net change in the charge on the node, $\Delta q_{\mathrm{A}}$. We also estimate the average net current into the node, $\bar{I}_{\mathrm{A}}$. Finally, as a first-order approximation, we estimate the switching time (i.e., the duration of the transient $\tau_{T}$ ) as

$$
\begin{equation*}
\tau_{T} \approx \frac{\Delta q_{\mathrm{A}}}{I_{\mathrm{A}}} \tag{16.6}
\end{equation*}
$$

where $\Delta q_{\mathrm{A}}$ is the net change in the charge on the mode and $\bar{I}_{\mathrm{A}}$ is the average net current into node A during the transient.

This method of estimating $\tau_{T}$ is fast and easy, and it is used in a wide variety of situations, as we shall see. It is most accurate, however, in cases where the
net current into the node, $i_{\mathrm{A}}$, is approximately constant over the major portion of the transient. In cases where the current varies continuously during the transient, it may be wise to also consider an alternative approach. For example, it may be possible to model the charge store as a linear capacitor during the transient. This is most reasonable if over the entire range between $V_{I}$ and $V_{F}$ the capacitance of the charge store, $d q_{A} / d v_{A B}$, is comparable to the ratio of $\Delta q_{A}$ to $\Delta v_{A B}$. If the capacitance is close to this ratio over most of the range, then we can approximate the charge store as a linear capacitor with value $C_{A}$, where

$$
\begin{equation*}
C_{\mathrm{A}} \equiv \frac{\Delta q_{\mathrm{A}}}{\Delta v_{\mathrm{AB}}} \tag{16.7}
\end{equation*}
$$

With this approximation we can write

$$
\begin{equation*}
\frac{d q_{\mathrm{A}}}{d v_{\mathrm{AB}}} \approx C_{\mathrm{A}} \quad \text { for } V_{I} \leq v_{\mathrm{AB}} \leq V_{F} \tag{16.8}
\end{equation*}
$$

and thus

$$
\begin{equation*}
\frac{d v_{\mathrm{AB}}}{d t} \approx \frac{i_{\mathrm{A}}}{C_{\mathrm{A}}} \quad \text { for } V_{I} \leq v_{\mathrm{AB}} \leq V_{F} \tag{16.9}
\end{equation*}
$$

Writing $i_{\mathrm{A}}$ in terms of $v_{\mathrm{AB}}$ yields a first-order differential equation for $v_{\mathrm{AB}}(t)$, which we can solve subject to the boundary condition that $v_{\mathrm{AB}}(0)=V_{I}$. Assuming that we can solve the differential equation (and this is not obvious because the equation may very well be nonlinear), this procedure gives us an expression for the waveform itself during the transient, as well as an estimate for the switching time $\tau_{T}$. [The time $\tau_{T}$ is $t$ such that $v_{\mathrm{AB}}(t)=V_{F}$.]

To summarize, we have seen that calculating the switching transients in circuits with elements that contain nonlinear charge stores is in general a formidable task, but we have also seen that in certain situations tractable approximations can be formulated. In particular, when the current is approximately constant during the transient, then the switching time is given approximately by the change in stored charge divided by the average current [i.e., by Eq. (16.6)]. When the node capacitance is approximately constant during the transient, then the switching transient can be approximated as the solution to a first-order differential equation [i.e., Eq. (16.9)]. In the following sections we will look at applications of these techniques to several specific examples, beginning with devices and then looking at several inverter circuits.

### 16.2 TURNING DEVICES ON AND OFF

We have studied two broad classes of transistors (i.e., bipolar and field effect), and each has its own distinct charge stores that play dominant roles in switching. We will look first at bipolar junction devices, beginning with the diode and then turning to the BJT. We will then look at field effect devices, taking the MOSFET as the most important representative. We will finish with a look at a surprising "new" (to us) field effect device, the isolated MOS capacitor.

### 16.2.1 Bipolar Junction Devices

In this section we consider devices in which a forward-biased $p-n$ junction plays a major role. The examples we choose are the $p-n$ junction diode and the bipolar junction transistor. As we know, there are two charge stores associated with any $p-n$ junction: the junction depletion region and the excess carrier populations. When changing the voltage across a $p$ - $n$ junction, charge must be added to or removed from both of these stores; this is what limits how fast a diode or transistor can be turned on or off.
a) $p$ - $n$ diodes. Consider the diode circuit shown in Fig. 16.1, which contains batteries, resistors, a three-position switch, and a diode. The switch is connected so that when it is down, the diode is unexcited (i.e., is in thermal equilibrium). When the switch is in its middle position, the diode is forward-biased; when the switch is in its upper position, the diode is reverse-biased.

Imagine, first, that after being in the lower, off position for a long time, the switch is put (at $t=0$ ) in the middle, forward-bias position. How long does it take the circuit to reach steady state? To answer this question, a good starting point is to consider the initial and final states. Initially the diode voltage and current are zero and the charge stored in the diode is that in the zero-biased depletion region.

At $t=0^{+}$, just after the switch is closed, the diode voltage remains zero (because the voltage across a charge store cannot change instantaneously) and the current jumps to $V_{S} / R_{S}$. Eventually, at times much greater than 0 , the diode voltage stabilizes at a value on the order of $V_{\mathrm{ON}}$ and the diode current $i_{D}$ is approximately $\left(V_{S}-V_{\mathrm{ON}}\right) / R_{S}$. If $V_{S}$ is much greater than $V_{\mathrm{ON}}$, then $i_{D}$ is essentially constant during the transient, $i_{A}$ will be approximately $V_{S} / R_{S}$, and we can hope to use Eq. (16.6) to estimate $\tau_{T}$.

To apply Eq. (16.6), we need to estimate $\Delta q_{\mathrm{A}}$. The main charge store in a forward-biased $p-n$ diode is in the excess carrier profiles. To calculate this charge we refer back to our discussion of diffusion capacitance in Sec. 7.3.4 and, specifically, to Eq. (7.41). A typical integrated-circuit diode, for example, will be a short-base, $n^{+}-p$ device, in which case we have

$$
\begin{equation*}
Q_{\mathrm{DF}}\left(V_{\mathrm{AB}}\right) \approx A q \frac{n_{i}^{2}}{N_{A p}}\left(e^{q V_{\mathrm{AB}} / k T}-1\right) \frac{w_{p}^{*}}{2} \tag{16.10a}
\end{equation*}
$$



FIGURE 16.1
Simple diode circuit containing batteries, resistors, a three-position switch, and a diode.
where $A$ is the area of the junction, $N_{A p}$ is the doping level on the $p$-side, and $w_{p}^{*}$ is the effective width of the $p$-side.* We use our quiescent notation to emphasize that we are dealing with transient switching between steady-state endpoints. This charge can also be written in terms of the diode current $I_{D}\left(V_{\mathrm{AB}}\right)$, which is approximately

$$
\begin{equation*}
I_{D}\left(V_{\mathrm{AB}}\right) \approx A q n_{i}^{2} \frac{D_{e}}{N_{A p} w_{p}^{*}}\left(e^{q V_{\mathrm{AB}} / k T}-1\right) \tag{16.11}
\end{equation*}
$$

Inserting Eq. (16.11) into Eq. (16.10a) yields

$$
\begin{equation*}
Q_{\mathrm{DF}}\left(V_{\mathrm{AB}}\right)=\frac{w_{p}^{* 2}}{2 D_{e}} I_{D}\left(V_{\mathrm{AB}}\right) \tag{16.10b}
\end{equation*}
$$

Applying Eq. (16.4a) to find $\Delta q_{A}$ we have

$$
\begin{equation*}
\Delta q_{A}=Q_{\mathrm{DF}}\left(V_{\mathrm{ON}}\right)-Q_{\mathrm{DF}}(0) \approx \frac{\left(w_{p}^{*}\right)^{2}}{2 D_{e}} I_{D}\left(V_{\mathrm{ON}}\right) \tag{16.12a}
\end{equation*}
$$

where $I_{D}\left(V_{\mathrm{ON}}\right)$ is $\left(V_{S}-V_{\mathrm{ON}}\right) / R_{S}$. Assuming that $V_{S}$ is large, so that $I_{D}\left(V_{\mathrm{ON}}\right)$ can be approximated as $V_{S} / R_{S}$, we then have

$$
\begin{equation*}
\Delta q_{\mathrm{A}} \approx \frac{\left(w_{p}^{*}\right)^{2}}{2 D_{e}} \frac{V_{S}}{R_{S}} \tag{16.12b}
\end{equation*}
$$

Returning to Eq. (16.6), and recognizing that $\bar{I}_{\mathrm{A}}$ is $V_{S} / R_{S}$, we have immediately

$$
\begin{equation*}
\tau_{T} \approx \frac{\left(w_{p}^{*}\right)^{2}}{2 D_{e}} \tag{16.13}
\end{equation*}
$$

This factor, $\left(w_{p}^{*}\right)^{2} / 2 D_{e}$, is often called the transit time $\tau_{\text {tr }}$ of the diode because it can be looked upon as the average time it takes an electron to transit the $p$-side of the device. To see this we note that the total number of electrons on the $p$-side of the diode when it is forward-biased is given approximately by

$$
\begin{equation*}
N_{\mathrm{TOT}} \approx-\frac{Q_{\mathrm{DF}}}{q} \tag{16.14}
\end{equation*}
$$

We then argue that the diode current $I_{D}$ should be this number divided by the average time an electron spends transiting the device, $\tau_{\mathrm{tr}}$, times the average charge on an electron, $-q$. Thus we must have

$$
\begin{equation*}
I_{D} \approx-\frac{q N_{\mathrm{TOT}}}{\tau_{\mathrm{tr}}}=\frac{Q_{\mathrm{DF}}}{\tau_{\mathrm{tr}}} \tag{16.15}
\end{equation*}
$$

[^27]Substituting this expression for $I_{D}$ into Eq. (16.12) yields

$$
\begin{equation*}
\tau_{\mathrm{tr}} \approx \frac{\left(w_{p}^{*}\right)^{2}}{2 D_{e}} \tag{16.16}
\end{equation*}
$$

In summary, we see that the diode turns on immediately in the sense that it conducts current in the forward direction as soon as the switch is closed, but there is a delay on the order of a minority carrier transit time $\tau_{\mathrm{tr}}$ before the excess carrier profiles are established and the diode reaches steady state. Notice also that the duration of the turn-on transient is independent of the final diode current. (You should think about that.)

Imagine now that the switch has been in the middle, forward-bias position for a long time and is suddenly moved at $t=0$ to the upper, reverse-bias position. In the final, steady state we know that the diode current will be negative and very small (that is, the diode current will be the reverse bias value, $-I_{s}$, which is approximately $-q_{A} n_{i}^{2} D_{e} / N_{A p} w_{p}^{*}$ ) and that the diode voltage will be $-V_{S}$.

At $t=0^{-}$, however, just before the switch is moved, the diode voltage is approximately $V_{O N}$ and it cannot change discontinuously when the switch is thrown. Thus at $t=0^{+}$the diode voltage must also be $V_{O N}$, and the diode current at $t=0^{+}$must be $-\left(V_{T}+V_{\mathrm{ON}}\right) / R_{S}$, which is negative and large. But does this make sense? Can the diode be conducting in the reverse direction?

A little thought and some consideration of the excess carrier profiles will show you that the diode can indeed conduct in the reverse direction, at least for a brief time after it has been switched from forward to reverse bias. The key point to realize is that the reason a diode does not conduct in the reverse direction in the steady state is that there are so few minority carriers on either side of the junction in the steady state that they cannot sustain a significant reverse current. Right after a $p-n$ junction has been forward-biased, however, there are plenty of minority carriers, and a large reverse current can flow until they are removed. The diagrams in Fig. 16.2 might help you see this. The situation at $t=0^{-}$is shown in Fig. 16.2a for our short-base, $n^{+}-p$ diode. The situation at $t=0^{+}$and for several times $t>0$ is shown in Fig. 16.2b.

Looking at Fig. 16.2b, we see that the excess carrier profile can support an electron diffusion current of $V_{S} / R_{S}$ until the voltage across the diode, and thus $n^{\prime}\left(0^{+}\right)$, is zero. Beyond that point, $n^{\prime}\left(0^{+}\right)$decreases to $-n_{p o}\left(=-n_{i}^{2} / N_{D p}\right)$, the diode starts to become reverse-biased, and the current falls toward zero. The two-step nature of the transient is illustrated in Fig. 16.2c.

During the initial portion of the transient, some electrons flow back across the junction and others continue to flow to the ohmic contact, where they recombine. These two currents are roughly the same and equal in magnitude to $V_{S} / R_{S}$, so the current discharging the charge store during this portion of the transient is approximately $2 V_{S} / R_{S}$, or twice the current during charging. Looking further at the distributions in Fig. 16.2b, we see (and you can show rigorously) that by the time $n^{\prime}\left(0^{+}\right)$is zero, two-thirds of the total excess carriers have been removed. Thus we can estimate that $\tau_{1}$, the duration of the first portion of the transient, is one-third of the turn-on delay (two-thirds of the total removed twice as fast); thus


## FIGURE 16.2

(a) Excess carrier profile in a forward-biased $n^{+}-p$ diode; ( $b$ ) excess carrier profile at several times shortly after the same diode has been reverse-biased using the circuit of Fig. 16.1; (c) the corresponding current transient.

$$
\begin{equation*}
\tau_{1} \approx \frac{\tau_{\mathrm{tr}}}{3}=\frac{w_{p}^{2}}{6 D_{e}} \tag{16.17}
\end{equation*}
$$

The second portion of the transient is more complex. It involves the removal and/or recombination of the remaining excess charge as well as the charging of the reverse-bias depletion region. Assuming that the former is still the dominant charge store, we can argue that the dynamics of the excess charge store will continue to dominate the transient and that one-half of the excess carriers will diffuse to the contact and recombine and one-half will diffuse to the now reversebiased junction and contribute to the current transient. The plane at $x=w / 2$ becomes a plane of symmetry for $t>\tau_{1}$, and we can anticipate that the time constant $\tau_{2}$ for the remaining transient is the transit time of a diode of width $w_{p} / 2$; that is,

$$
\begin{equation*}
\tau_{2} \approx \frac{1}{2 D_{e}}\left(\frac{w_{p}}{2}\right)^{2}=\frac{\tau_{\mathrm{tr}}}{4} \tag{16.18}
\end{equation*}
$$

Perhaps the most important lesson to be gained from this discussion is the realization that a forward-biased $p-n$ junction diode cannot be turned off immediately and that the excess carrier charge store plays the dominant role in determining the transient. This knowledge, in turn, helps us to design a fasterswitching diode. For example, it is clear that an $n^{+}-p$ diode will be faster than a $p^{+}-n$ diode because $D_{e}$ is larger than $D_{h}$. Also, it is clear that the narrower we make the $p$-region, the better.

When a $p-n$ diode is needed in a bipolar integrated circuit, an $n p n$ transistor is usually used. This is done (1) because $n p n$ transistors are the device for which the fabrication process has been optimized and they are readily available, and (2) because $n p n$ transistors make excellent diodes. To see how and why, consider the several possible connections of a BJT as a diode shown in Fig. 16.3. A little thought should show you that the emitter-base diode will be faster than the Basecollector diode because it is an $n^{+}-p$ diode and because $w_{B}$ is typically much less than $w_{C}$. Assuming then that we choose the emitter-base diode, there is still a question as to what we do with the base-collector diode. Clearly we do not want to connect the collector to the emitter as shown in Fig. $16.3 a$ because then the slow base-collector diode would dominate the switching transient, but should the collector be left unconnected as in Fig. $16.3 b$ or be shorted to the base as in Fig. $16.3 c$ ? It is an instructive exercise to convince yourself that the latter is by far the better choice. (See also Problem 16.1.) Interestingly, the full transistor is needed to get the best diode.
b. Bipolar transistors. The first issue to address as we now consider turning BJTs on and off is how we reconcile the methodology we presented earlier, which subtly implied we were dealing with only a pair of terminals and a single charge store, with a three-terminal device with multiple charge stores like a transistor. The answer is that although transistors have three terminals, the charging and discharging of the dominant charge stores occur primarily through only one pair of terminals and that our methodology works just fine. This will become clear as we proceed with our analysis.

Consider, then, using the same voltage source, resistor, and switch we used to turn our diode on and off to now turn an npn BJT on and off. The connection


FIGURE 16.3
Three possible interconnections of an npn BJT as a diode: (a) emitter and collector junctions in parallel; $(b)$ collector terminal open-circuited; (c) base-collector junction shorted.
is illustrated in Fig. 16.4. When the switch is in the lower position, the device is off, with no bias on the base-emitter junction. When the switch is in the middle position, the base-emitter junction is forward-biased and the BJT will be turned on. When the switch is all the way up, the BJT will be turned off, with the baseemitter junction reverse-biased. The question again is how quickly does all this happen?

Assume that the switch is initially in the lower position and at $t=0$ is moved to the middle position. The steady-state base current will be approximately $\left(V_{S}-V_{\mathrm{ON}}\right) / R_{S}$, and the steady-state collector current will be $\beta_{F}$ times larger, or $\beta_{F}\left(V_{S}-V_{\mathrm{ON}}\right) / R_{S}$. Assuming that when on, the transistor is in its forward active region and is not saturated (we will consider saturation shortly), then the main charge store that has to be built up during the turn-on transient is that in the base. This is illustrated in Fig. 16.5a. There is also charge stored in the depletion regions associated with each junction, which we are not including in our analysis. The assumption is that a modern, integrated digital BJT is designed to minimize the junction capacitances and, more importantly, is operated at sufficiently high current densities that the excess carrier charge stores are dominant.

Recalling our diode discussion, particularly Eq. (16.12a), we realize that the excess charge store in the base, $Q_{B}$, can be written as

$$
\begin{equation*}
\Delta q_{A}=Q_{B}=\frac{I_{C} w_{B}^{2}}{2 D_{e}}=\frac{\beta_{F} I_{B} w_{B}^{2}}{2 D_{e}} \tag{16.19}
\end{equation*}
$$

The holes in this store are supplied through the base current; the electrons are supplied through the emitter.

Assuming that $V_{S}$ is much greater than $V_{\mathrm{ON}}$, the base current will be essentially constant, at its steady-state value $I_{B}$, which we have said is approximately $\left(V_{S}-V_{O N}\right) / R_{S}$ over the entire turn-on transient; thus we can use Eq. (16.6) to estimate the turn-on switching time to be


FIGURE 16.4
Simple bipolar transistor circuit to illustrate the switching transients encountered when turning a BJT on and off,


FIGURE 16.5
Excess charge stores within an npn bipolar transistor: (a) biased in the forward active region with a base current $V_{S}^{\prime} / R_{S} ;(b)$ biased into saturation with equal base and collector currents of $V_{S} / R_{S}$ [the values of $V_{S}$ and $R_{S}$ are of course different from (a)]; (c) the same charge stores illustrated for an $n$ pn bipolar transistor biased as in (b) but with a Schottky diode clamp on the base-collector junction. In the graphs $w_{E}=w_{B}=w_{C}, \mu_{e}=3 \mu_{h}$, and $N_{D E}=10 N_{A B}=100 N_{D E}$.

$$
\begin{equation*}
\tau_{T} \approx \frac{\Delta q_{A}}{I_{B}}=\frac{\beta_{F} B w_{B}^{2}}{2 D_{e}}=\beta_{F} \tau_{B} \tag{16.20}
\end{equation*}
$$

where $\tau_{B}$ is the base transit time $w_{B}^{2} / 2 D_{e}$. Comparing this result to the turn-on time of a diode, Eq. (16.13), we find that it is $\beta_{F}$ times longer! In fact, the situation is even somewhat worse than this because as $i_{C}$ builds up, a larger and larger fraction of the base current goes into feeding recombination in the base and less is available to charge the base.

Clearly, turning a high-gain transistor on using the steady-state base current is a relatively slow process. There are two possible ways around this problem. The first is to find a way to make the base current large until the transistor is turned on and to then reduce it to a smaller, steady-state value. Emitter-coupled logic (ECL) relies on this approach (as well as on never turning the transistors fully off). The second is to drive the device with a large steady-state base current that forces it into saturation and effectively reduces $\beta_{F}$. This is what is done in transistor-transistor logic (TTL), * but it is not without its problems. There is additional charge storage associated with saturating a bipolar junction transistor. In particular, when a BJT is in saturation, its base-collector junction is forwardbiased, minority carriers are injected into the collector, and there is considerably more charge storage (i.e., $\Delta q_{A}$ is much larger). We will analyze this situation next.

To see how long it takes to turn a BJT on when driving it into saturation, let us look at our circuit in Fig. 16.4 with $V_{C C}=V_{S}$ and $R_{C}=R_{S}$. When the switch is in the on position, the transistor saturates with $I_{B} \approx V_{S} / R_{S}, I_{C} \approx V_{S} / R_{S}$, and $I_{E} \approx-2 V_{S} / R_{S}$. The forward bias current crossing the emitter-base junction is thus $2 V_{S} / R_{S}$ and consists mainly of electrons injected into the base. A little work with the Ebers-Moll model shows us that the current of electrons injected from the emitter into the base, assuming negligible base recombination, is actually ( $\left.2-\alpha_{R}\right)\left[\alpha_{F} /\left(1-\alpha_{F} \alpha_{R}\right)\right]\left(V_{S} / R_{S}\right)$, but this reduces to $2 V_{S} / R_{S}$ if we assume $\alpha_{F}$ is nearly 1 , and $\alpha_{R}$ is small. Consequently, the charge stored in the base, $Q_{B}$, is

$$
\begin{equation*}
Q_{B} \approx \frac{2 V_{S}}{R_{S}} \frac{w_{B}^{2}}{2 D_{e}} \tag{16.21}
\end{equation*}
$$

This is illustrated in Fig. 16.5b.
The forward bias current across the base-collector junction is the "excess" base current, $I_{B}-I_{C} / \beta_{F}$, which in the present example is $\left(1-1 / \beta_{F}\right) V_{S} / R_{S}$, or essentially $V_{S} / R_{S} ;{ }^{\dagger}$ it consists primarily of holes injected from the base into the collector. We can use the Ebers-Moll model to find the precise fraction of this current that is holes injected into the collector; doing this we find that the fraction

[^28]is $\left(2 \alpha_{F}-1\right)\left(1-\alpha_{R}\right) /\left(1-\alpha_{F} \alpha_{R}\right)$, which is approximately 1 when $\alpha_{F}$ is close to 1 and $\alpha_{R}$ is small. Thus the charge store in the collector, $Q_{C}$, is
\[

$$
\begin{equation*}
Q_{C} \approx \frac{V_{S}}{R_{S}} \frac{w_{C}^{2}}{2 D_{h}} \tag{16.22}
\end{equation*}
$$

\]

Fig. $16.5 b$ illustrates this also.
All of this stored charge, $Q_{B}$ and $Q_{C}$, is supplied by the base current, so in the notation of Eq. (16.6) we have

$$
\begin{align*}
\Delta q_{A} & =Q_{B}+Q_{C}  \tag{16.23}\\
\vec{I}_{A} & =\frac{V_{S}}{R_{S}} \tag{16.24}
\end{align*}
$$

Combining these last four equations in Eq. (16.6) yields

$$
\begin{equation*}
\tau_{T}=2 \frac{w_{B}^{2}}{2 D_{e}}+\frac{w_{C}^{2}}{2 D_{h}} \tag{16.25a}
\end{equation*}
$$

which is twice the base transit time $\tau_{B}$ plus the collector transit time $\tau_{C}$; that is,

$$
\begin{equation*}
\tau_{T}=2 \tau_{B}+\tau_{C} \tag{16.25b}
\end{equation*}
$$

This result again is independent of the magnitude of the base current; it does depend quantitatively on the fact that we assumed that the transistor is in a circuit with $V_{C C}=V_{S}$ and $R_{C}=R_{S}$ so that in saturation $I_{C}=I_{B}$, but the basic elements are the same whatever the bias condition and level of saturation.

Now it is time to step back and see what driving the transistor into saturation has gotten us or has cost us. We certainly have reduced the time it takes to charge the base from $\beta_{F} \tau_{B}$ to $2 \tau_{B}$, but we have added the collector transit time, which can be substantial. The factor $D_{h}$ in the denominator is roughly $D_{e} / 3$, so even if $w_{C} \approx w_{B}$, then $\tau_{C}$ is approximately $3 \tau_{B}$ and thus $\tau_{T}$ is approximately $5 \tau_{B}$. More realistically, $w_{C}$ will be 3 to 4 times $w_{B}$, so $\tau$ is 10 to 16 times $\tau_{C}$ and $\tau_{T}$ is more likely to be 30 or more times $\tau_{B}$. We don't seem to have gained much.

The ultimate solution to this dilemma is to shunt the base-collector junction with a diode that has a smaller turn-on voltage and less charge storage associated with it. Then when the base-collector terminals become forward-biased, the current flows through this shunting diode and not across the base-collector junction. A metal-semiconductor, or Schottky diode, is the perfect choice for this shunting diode because it has a relatively small turn-on voltage and no excess charge store; Schottky clamps are widely used in TTL to eliminate $Q_{C}$ (see App. E). In such cases, the excess current input at the base (i.e., $V_{S} / R_{S}-I_{\mathcal{C}} / \beta_{F}=V_{S} / \beta_{F}$ ) flows through the Schotky diode and into the collector terminal in the steady state, and the total collector current is $V_{S} / R_{S}$ plus this amount, or essentially $2 V_{S} / R_{S}$. Correspondingly, minority carrier injection occurs only at the emitter-base junction, and the associated charge store $Q_{B}$ is that due to an emitter current of $2 V_{S} / R_{S}$ as illustrated in Fig. 16.5c. $Q_{B}$ is again given by Eq. (16.21), and this charge is again supplied by the base current, which (initially at least) is $V_{S} / R_{S}$. We say "initially at least" because as the transistor
tries to saturate, some of this current is shunted through the Schottky diode and is no longer available to charge up $Q_{B}$ in the base. Ignoring this complication, we find that $\tau_{T}$ is approximately $2 \tau_{B}$. Thus we have been able to eliminate $\tau_{C}$, and $\tau_{T}$ is the smallest we have seen so far.

Next consider the problem of turning a BJT off. All of the excess charge must be removed before the device will turn off and the collector current will drop to zero. In our circuit in Fig. 16.4, suppose we suddenly move the switch from the middle position to the up position. At first a negative base current of approximate magnitude $V_{S} / R_{S}$ flows, removing holes from the base and, if the device is saturated, from the collector. More dramatically, because of all of the excess carriers in the device, the collector current will continue to flow and will be essentially unchanged until the excess populations at the junctions fall to zero, as was much the case in the $p-n$ diode. Only then will the collector current begin to decrease. This behavior is illustrated in Fig. 16.6.

First consider the situation when the transistor is not saturated. In this case the negative base current $-V_{S} / R_{S}$ flows, removing holes from the base. At the same time, however, the much larger collector current will continue to flow, also removing charge from the base. As we have said, the collector current will remain at its initial level, which in this case is $\beta_{F} V_{S} / R_{S}$, until the excess population at the base-emitter junction drops to zero. When this happens, roughly two-thirds of the excess charge will have been removed. The time it takes for this to occur is $2 Q_{B} / 3 I_{C}$, or $2 \tau_{B} / 3$. (Notice that this is considerably less time than the time, $\beta_{F} \tau_{B}$, it took for the base current to charge up the base.) After this time, the collec-


FIGURE 16.6
Qualitative sketch of the collector current as an $n p n$ bipolar transistor is switched from an unbiased state to a forward-biased state and then is switched off with a reverse bias applied to the base-emitter junction.
tor current decreases to zero and the transistor starts to really turn off. Beyond this point the remaining collector current will continue to be the main mechanism discharging $Q_{B}$, but the rate of discharge will be reduced and the transient will have a long tail.

If the transistor had been turned on so strongly that it was saturated, as in Fig. $16.5 b$, then the collector current will continue to flow until both $Q_{B}$ and $Q_{C}$ are removed. Now, however, we have a larger base current (i.e., $V_{S} / R_{S}$ in our example) aiding the collector current in removing the stored charge. Using the same arguments as above, we conclude that since we have a total current of $2 V_{S} / R_{S}$ discharging a charge store of $Q_{B}+Q_{C}$, with $Q_{B}$ and $Q_{C}$ given by Eqs. (16.21) and (16.22), respectively, the current will remain constant for roughly $\left(2 \tau_{B}+\tau_{C}\right) / 3$ and will then decay to zero, this time with a somewhat shorter tail.

Finally, if the base-collector junction had been clamped with a Schottky diode, there would be no $Q_{C}$ to remove and we would need to remove only $Q_{B}$, just as was the case with a transistor initially biased in its forward active region. An important difference, however, is that we now have a relatively much larger base current helping the collector current discharge $Q_{B}$, just as we did with the transistor driven into saturation. Since the magnitude of this $I_{B}$ is comparable to that of $I_{C}$ (e.g., both are $V_{S} / R_{S}$ in our example), the rate of discharge will be doubled and $I_{C}$ will remain constant only half as long (i.e., for only a time of roughly $\tau_{B} / 3$ ) and will then fall to zero more quickly. The overall turn-off transient may well be less than $\tau_{B}$.

Note that in all of these cases, if more current can be drawn out of the base, the transient can be reduced correspondingly. We will see how this observation is used to increase the speed of bipolar logic circuits when we study TTL in Sec. 16.3.2.

### 16.2.2 Field Effect Devices

The dominant charge store in a field effect device is that associated with the gate electrode; it is the gate current that supplies this charge and determines the switching time. This is true of all field effect devices, but we will focus on the MOSFET because it is by far the most important FET; our treatment can be easily extended to other types of FETs. In the second part of this section, we will also look at a "new" device, the isolated MOS capacitor, and will learn how a modern video camera sees.
a) MOSFETs. A MOSFET is turned on or off by charging or discharging its gate, and this is done with the gate current. We normally do not think of the gate current of a MOSFET because in the steady state $i_{G}$ is zero, but when the voltage on the gate is changing, the gate current is the whole story and is definitely not zero.

The variation of the gate charge with the gate voltage depends on the condition of the channel. Below threshold, the gate "capacitor" looks like a linear parallel-plate capacitor $C_{O X}$ in series with a nonlinear depletion region charge store and the charge on the gate is a nonlinear function of $v_{G S}$. To the extent that there is a physical overlap between the gate metal and the drain region (e.g.,
the $n^{+}$-region in an $n$-channel device), there will also be a parallel charge store that is linearly dependent on the gate-to-drain voltage $v_{G D}$, but this should be very small in a modern self-aligned MOSFET.*

Above threshold the charge on the gate, $q_{G}$, can be written as [see Sec. 14.3.2, Eq. (14.42)]

$$
\begin{equation*}
q_{G}=Q_{\mathrm{TH}}+\frac{2}{3} W L C_{\mathrm{OX}}^{*}\left(v_{G S}-V_{T}\right) \tag{16.26}
\end{equation*}
$$

when the MOSFET is in saturation and as

$$
\begin{equation*}
q_{G}=Q_{\mathrm{TH}}+\frac{2}{3} W L C_{\mathrm{OX}}^{*} \frac{\left(v_{G S}-V_{T}\right)^{3}-\left(v_{G D}-V_{T}\right)^{3}}{v_{G D}^{2}-2 V_{T}\left(v_{G D}-v_{G S}\right)-v_{G S}{ }^{2}} \tag{16.27}
\end{equation*}
$$

when the MOSFET is in the linear, or triode, region. $Q_{\text {TH }}$ in Eqs. (16.26) and (16.27) is the gate charge at threshold. In deriving these expressions we have assumed that $v_{B S}$ is zero and that variations in the depletion region charge along the channel are negligible. Notice also that we have written Eq. (16.27) in terms of $v_{G S}$ and $v_{G D}$, rather than $v_{G S}$ and $v_{D S}$, because we are thinking in terms of the charge on the gate and thus want to consider the voltage on the gate relative to the other terminals.

Looking first at Eq. (16.26), we see that when the MOSFET is in saturation, the gate charge store looks like an ideal parallel-plate capacitor $2 C_{G} / 3$, where $C_{G}$ is $W L C_{\mathrm{OX}}^{*}$, and that the charge increases linearly with the gate voltage in excess of threshold [i.e., with $\left(v_{G S}-V_{T}\right)$ ]. This is a very important and convenient result.

If the MOSFET is not saturated (i.e., if it is in its linear or triode region), the gate charge is a more complex function of both $v_{G S}$ and $v_{G D}$. Closer examination of the capacitance between the gate and source, $d q_{G} / d v_{G S}$, and between the gate and drain, $d q_{G} / d v_{G D}$, showed us in Chap. 14 [see Eqs. (14.48) to (14.51) in Sec. 14.3.2] that when $\nu_{D S}$ is small, the gate charge varies as $\left(C_{G} / 2\right) v_{G D}$ and as $\left(C_{G} / 2\right) v_{G S}$; whereas when $v_{D S}$ is near saturation (i.e., $v_{D S} \approx v_{G S}-V_{T}$ and thus $v_{G D} \approx V_{T}$ ), the gate charge varies as ( $2 C_{G} / 3$ ) $v_{G S}$ and does not vary appreciably with $v_{G D}$.

The capacitance of the gate is clearly a nonlinear function of the gate voltage when a MOSFET is in its linear region. Nonetheless, a convenient, worst-case approximation is to assume that the capacitance is linear and constant, just as it is in saturation, and to say that when the MOSFET is in the linear region

$$
\begin{equation*}
q_{G} \approx Q_{\mathrm{TH}}+\frac{2}{3} C_{G}\left(v_{G S}-V_{T}\right)+\frac{1}{3} C_{G}\left(v_{G D}-V_{T}\right) \tag{16.28}
\end{equation*}
$$

Being able to model a charge store as linearly dependent on the terminal voltages is a major simplification and allows us to use Eq. (16.9) to determine

[^29]

FIGURE 16.7
Simple circuit used to illustrate the switching transients encountered in turning a MOSFET on and off.
the switching transient [along with Eq. (16.6) if the charging current is constant]. To see how this works consider the circuit shown in Fig. 16.7.

With the switch in the lowest position the MOSFET is biased just at threshold and is essentially off and $v_{\text {OUT }} \approx V_{S}$. Using this starting point lets us ignore the transient involved with charging the gate to threshold; this should be a negligible delay in a well-designed circuit, so ignoring it is reasonable.

Next assume we move the switch to the middle position at $t=0$. The transistor will be in saturation initially with $v_{G S}=V_{T}$ and $v_{\text {OUT }}=V_{S}$. The gate charge varies linearly with $y_{G S}$ according to Eq. (16.26), so the charging occurs with an RC time constant of $2 R_{S} C_{G} / 3$ and $v_{G S}$ varies with time as

$$
\begin{equation*}
v_{G S}(t)=V_{T}+\left(V_{S}-V_{T}\right)\left(1-e^{-3 t / 2 R_{S} C_{G}}\right) \tag{16.29}
\end{equation*}
$$

Simultaneously, vout increases since $v_{\text {OUT }}$ is $\left(V_{S}-i_{D} R_{D}\right)$, where $i_{D}(t)$ is $K\left[v_{G S}(t)-V_{T}\right]^{2} / 2$.

This transient continues until $v_{\text {OUT }}=\left(v_{G S}-V_{T}\right)$, at which time the device enters its linear region and the capacitance of the gate increases and the rate of charging decreases somewhat. The largest this capacitance becomes is $C_{G}$, however, or only 33 percent higher, so the error in assuming the same transient for $v_{G S}(t)$ is modest.* Alternatively, we could use $C_{G}$ rather than two-thirds $C_{G}$ for the entire transient; this is often what is done.

[^30]Whatever fraction is used, the lesson to be learned is the same: The total gate oxide capacitance $C_{G} \equiv W L C_{\mathrm{ox}}^{*}$ is the critical device parameter. The smaller the gate area $(=W L)$ and the smaller the value of $C_{0 x}^{*}\left(=\varepsilon_{o} / x_{o}\right)$, the faster the MOSFET can be turned on through a given source resistance $R_{S}$.

Another important lesson to be learned about MOSFET switching is that, in contrast to the situation with BJTs, the smaller the value of $R_{S}$ and/or the larger the gate charging current, the faster a MOSFET can be switched.

The turn-off transient is pretty much the same as the turn-on transient in reverse. The gate charge must be discharged to turn the MOSFET off, and if the switch is returned to this initial position, the discharge will proceed with an exponential decay having a time constant of approximately $R_{S} C_{G}$.

We will have a good deal more to say about MOSFET transients in Sec. 16.3.1 when we look at various MOSFET inverters, and you may want to proceed directly there. You will find the next section interesting, too, however, so read it eventually.
b) Isolated MOS capacitors and charge-coupled devices. All of the MOS structures we have considered thus far have included adjacent, heavily doped regions that can readily supply the inversion layer carriers. An interesting situation arises if we do not have these regions but instead simply have an isolated MOS capacitor like that illustrated in Fig. 16.8. Now if we suddenly apply a voltage greater than $V_{T}$ between the gate and the substrate, an inversion layer cannot form quickly since there are very few minority carriers (electrons in the case of Fig. 16.8) in the substrate. Instead what happens initially is that all of the charge induced in the semiconductor is in the form of ionized acceptors in a depletion region that is now wider than the $X_{D T}$ we defined in Chap. 9. The steady-state depletion region width is still $X_{D T}$, but initially the structure is not in its steady-state condition. The corresponding net charge, electric field, and electrostatic potential distributions are shown in Figs. 16.9a, b, and c. Going through the type of depletion approximation


FIGURE 16.8
Cross-sectional drawing of an isolated MOS capacitor fabricated on a $p$-type silicon substrate.


FIGURE 16.9
( $a, b, c$ ) The net charge, electric field, and electrostatic potential profiles, respectively, through an isolated MOS capacitor immediately after the application of a bias voltage $v_{G B}$ that exceeds the threshold $V_{T} ;(d, e$, and $f)$ the same quantities at a much later time.
calculations we did in Chap. 9 to relate the charge and voltage in such structures, we find that the depletion region width $x_{D}$ is the solution to the quadratic equation obtained by adding the change in electrostatic potential across the oxide and in the semiconductor (i.e., across the depletion region) and setting this sum equal to the voltage on the gate in excess of the flat-band voltage:

$$
\begin{equation*}
v_{G B}-V_{\mathrm{FB}}=\frac{q N_{A p} x_{D}^{2}}{2 \varepsilon_{\mathrm{Si}}}+\frac{t_{o}}{\varepsilon_{o}}\left(q N_{A p} x_{D}+\left|q_{N}^{*}\right|\right) \tag{16.30}
\end{equation*}
$$

The first term on the right-hand side of the equation is the voltage drop in the semiconductor, and the second is the drop across the oxide. Initially, of course, the inversion layer charge $q_{N}^{*}$ is zero, so the relationship right after application of $v_{G B}$ is

$$
\begin{equation*}
v_{G B}-V_{\mathrm{FB}}=\frac{q N_{A p} x_{D}^{2}}{2 \varepsilon_{\mathrm{Si}}}+\frac{t_{o}}{\varepsilon_{o}}\left(q N_{A p} x_{D}\right) \tag{16.31}
\end{equation*}
$$

Solving this for $x_{D}$, we find

$$
\begin{equation*}
x_{D}=\sqrt{\left(\frac{\varepsilon_{\mathrm{Si}} t_{o}}{\varepsilon_{0}}\right)^{2}+\frac{2 \varepsilon_{\mathrm{Si}}}{q N_{A P}}\left(V_{G B}-V_{\mathrm{FB}}\right)}-\frac{\varepsilon_{\mathrm{Si}} t_{o}}{\varepsilon_{o}} \tag{16.32}
\end{equation*}
$$

The sheet charge density on the gate is equal and opposite to the depletion region charge, which is simply this width times $-q N_{A p}$; that is,

$$
\begin{equation*}
q_{G}^{*}=q N_{A p} x_{D} \tag{16.33}
\end{equation*}
$$

With time an inversion layer will build up and the structure will reach its steady-state condition, which is identical to that of an MOS capacitor with an adjacent $n^{+}$-region to supply the electrons. This is illustrated in Figs. 16.9d, e, and $f$. As the inversion layer charge is building up, the depletion region width decreases as

$$
\begin{equation*}
x_{D}=\sqrt{\left(\frac{\varepsilon_{\mathrm{Si}} t_{o}}{\varepsilon_{o}}\right)^{2}+\frac{2 \varepsilon_{\mathrm{Si}}}{q N_{A p}}\left(v_{G B}-V_{\mathrm{FB}}-\frac{t_{o}}{\varepsilon_{o}}\left|q_{N}^{*}\right|\right)}-\frac{\varepsilon_{\mathrm{Si}} t_{o}}{\varepsilon_{o}} \tag{16.34}
\end{equation*}
$$

and the gate charge, which is now equal in magnitude to the inversion layer charge plus the charge in the depletion region, increases as

$$
\begin{equation*}
q_{G}^{*}=\left|q_{N}^{*}\right|+q N_{A p} x_{D} \tag{16.35}
\end{equation*}
$$

with $x_{D}$ given by Eq. (16.34). The inversion layer sheet charge density can increase until the depletion region width decreases to $x_{D T}$, at which point it will be $-\left(v_{G B}-V_{T}\right) \varepsilon_{o} / t_{o}$. That is, $\left|q_{N}^{*}\right|$ has the following bounds:

$$
\begin{equation*}
0 \leq\left|q_{N}^{*}\right| \leq\left(v_{G B}-V_{T}\right) \frac{\varepsilon_{o}}{t_{o}} \tag{16.36}
\end{equation*}
$$

The key question is where do the electrons in the inversion layer of an isolated MOS capacitor come from? The answer is from several possible places. One such place is from the substrate bulk. Minority carriers from the bulk can diffuse to the edge of the depletion region and be swept to the oxide-silicon interface, where they accumulate in the inversion region. This is analogous to the reverse-bias current in a $p-n$ diode and has a magnitude

$$
\begin{equation*}
i_{1}=q_{\mathrm{A}} \frac{n_{i}^{2}}{N_{A_{p}}} \frac{D_{e}}{L_{e}} \tag{16.37}
\end{equation*}
$$

A second source of electrons is generation in the depletion region, and a third source is generation at the oxide-semiconductor interface. We separate these two generation sources because the minority carrier lifetime is typically shorter, and thus the generation is somewhat higher, at the interface than in the bulk. In a modern device, however, neither of these generation mechanisms is as important as the first mechanism (i.e., diffusion from the bulk).

To estimate how long it takes to reach equilibrium, suppose we apply a bias 1 V in excess of threshold to an isolated MOS capacitor with $t_{o}=40 \mathrm{~nm}, N_{A p}=$ $10^{16} \mathrm{~cm}^{-3}, D_{e}=40 \mathrm{~cm}^{2}$, and $L_{e}=2 \times 10^{-2} \mathrm{~cm}$. The $\Delta q_{\mathrm{A}}$ is $A C_{\mathrm{ox}}^{*}\left(v_{G S}-V_{T}\right)$, which is $9 \times 10^{-7} \mathrm{C} / \mathrm{cm}^{2}$. The charging current $\bar{I}_{\mathrm{A}}$ is $i_{1}$, which turns out to be $2.7 \times 10^{-12} \mathrm{~A} / \mathrm{cm}^{2}$. Thus, using Eq. (16.6), we find that $\tau_{T}$ is $3 \times 10^{5} \mathrm{~s}$, or roughly 100 hours!*

Looking at this result (i.e., that it takes a relatively long time for an inversion layer to accumulate under an isolated MOS gate), device researchers soon realized that this structure could form the basis of a very sensitive light detector. Light incident in or near the depletion region will generate hole-electron pairs, and the electrons will collect in the inversion layer, building it up relatively quickly. The more intense the light, the faster the inversion layer builds up.

What is needed next is a method for sensing how much charge is in the inversion layer of a given isolated MOS capacitor. There are several ways to do this, but the most interesting and significant methods involve first moving the charge to another MOS capacitor structure or, better yet, through a series of "isolated" MOS capacitors. The process of moving the charge is illustrated in Fig. 16.10.

Suppose that the left-most MOS capacitor in Figure 16.10 is biased above threshold with a holding voltage $V_{\mathrm{Ho}}$ and is illuminated briefly so that an inversion layer forms under it. If an even larger transfer voltage $V_{\text {Tr }}$ is applied to the adjacent MOS capacitor to its right and if the two structures are sufficiently close together, the inversion layer charge of the first structure will be drawn under the second. If the bias on the first electrode is then reduced to zero and the bias on the second electrode is reduced to $V_{\mathrm{H}}$, the optically injected charge will have been moved one step to the right. If the process is now repeated with the next electrode, the charge can be moved one more step to the right. This process can be repeated over and over, moving the charge to the right through the chain of electrodes.

Strings of MOS capacitors designed to pass charges along like this are called charge-coupled devices, or CCDs. The individual MOS capacitors are often designed so that the charge sits to one side; they are connected in two sets that are biased alternately to move the charge along. Fig. $16.11 a$ shows an example where each capacitor is a composite of two gates, each with a different threshold.

Two-dimensional arrays of CCDs can clearly also be formed that, when exposed to an image, translate the image into an array of variously charged inversion layers, as shown in Fig. 16.11b. By shifting the charge to the right, into another vertical CCD, which in turn shifts it downward, the image can be "scanned" out as a sequence of charge packets, each of which corresponds to one point, or pixel, of the image. The total amount of charge in each packet represents the intensity of the image at the corresponding pixel location. Notice that since the vertical

[^31]
(a)

(b)

(c)

(d)

FIGURE 16.10
Process of moving the charge in the inversion layer from one MOS capacitor to the next: (a) optical injection of a packet of charge under an MOS capacitor biased with a holding voltage $V_{\mathrm{Ho}} ;(b)$ the initially biased electrode shown with its charge packet; (c) the larger transfer voltage $V_{\mathrm{Tr}}$ applied to an adjacent electrode, to which the charge is attracted; (d) the bias on the first electrode reduced to zero and that on the second electrode reduced to the holding voltage $V_{\mathrm{Ho}}$, completing the transfer cycle. The dotted lines indicate the maximum extent of the depletion region and give some indication of the attraction of the electrode for charge.
Charge-coupled devices: (a) a linear two-phase CCD shift register; (b) the layout of a
two-dimensional CCD array of the type that might be used in an image sensor. (q) II'9I THODIA (q)


CCD is collecting information from all of the rows, it must be operating at a much faster rate than the row CCDs. It must shift all of its information out before another set of charges is shifted into it from the row CCDs.

So far we have succeeded only in moving the charge around, but have not yet sensed, or "read," it. There are several mechanisms by which the amount of charge in an inversion layer can be sensed. A simple technique is to use a reverse-biased $n^{+}$-region placed adjacent to the last electrode in the chain, as shown in Fig. 16.12a. If there are electrons in the inversion layer, they will be swept across the reverse-biased junction and will appear as a voltage pulse across the resistor; if the inversion layer is empty, no current will flow. A problem with this technique is that the charge packets are small and therefore the current pulses are small. Making the resistor larger increases the size of the voltage pulse, but slows the response because the RC time constant of the circuit is longer.

A better approach than using a large sensing resistor is to connect the $n^{+}-$ region to the gate of a MOSFET and precharge the $n^{+}$-region and gate to some voltage $V_{P C}$ that is sufficient to turn the MOSFET on, as shown in Fig. 16.12b. Then when the inversion layer charge packet is moved under the electrode adjacent to the junction, any electrons in it will flow across the junction, partially discharging the node and reducing the conductivity of the MOSFET. By sensing the MOSFET current, we can deduce the size of the charge packet. We then re-precharge the node and wait for the next packet. This method has the virtue of having gain because using a MOSFET in this way amplifies the effect of the charge packet. For best results this scheme is usually used with the MOSFET as part of a high-gain differential amplifier stage, and the whole package is then called a sense amplifier. Similar circuits are used to read MOS memories.

A final important observation is that the charge need not be removed from the inversion layer, as it is in the two schemes just described, to be detected. It can be read nondestructively by precharging a "sense" electrode to a sufficient voltage that any charge in the inversion layer of the adjacent final CCD electrode will be attracted to it . When a charge packet arrives at the last stage of the CCD, it will be attracted to the sense electrode and will change its voltage. That it will have this effect may not at first be obvious to you, but to see what happens, first realize that the precharging process places a certain amount of sheet charge, $Q_{G}^{*}$, on the electrode. Since the electrode is then isolated and the amount of charge on it cannot change, the amount of charge under it in the semiconductor cannot change either. Nonetheless, when a charge packet arrives, a corresponding amount of charge under the electrode will effectively move from the depletion region to the inversion layer (i.e., closer to the gate) and the voltage on the gate (relative to the substrate) will decrease. We can calculate by how much by setting $q_{G}^{*}$ in Eq. (16.35) equal to $Q_{\mathrm{G}}^{*}$ and solving for $v_{G B}$. The change in voltage, $\Delta v_{G B}$, is the difference between $v_{G B}$ with $q_{N}^{*}$ equal to the charge in the charge packet and $V_{G B}$ with $q_{N}^{*}$ equal to zero; we find

$$
\begin{equation*}
\Delta v_{G B}=-\frac{2 Q_{G}^{*}\left|q_{N}^{*}\right|-\left|q_{N}^{*}\right|^{2}}{2 \varepsilon_{S i} q N_{A p}} \tag{16.38}
\end{equation*}
$$



FIGURE 16.12
Three methods of sensing a charge packet in a CCD shift register: (a) a reverse-biased $p$ - $n$ junction diode in series with a resistor; $(b)$ a reverse-biased $p-n$ junction connected to a precharged MOSFET gate; (c) a precharged electrode connected to a MOSFET gate. The latter method does not destroy the charge packet, whereas the first two are destructive processes.

This decrease, which for small $\left|q_{N}^{*}\right|$ varies linearly with $\left|q_{N}^{*}\right|$ can be sensed using a MOSFET as shown in Fig. 16.12c. A virtue of this technique is that it does not destroy the charge packet, and the packet can be moved into another CCD train if so desired. This feature is most important in certain linear signal processing applications of CCDs; it is less important for image processing.

Charge-coupled devices are very useful structures, and their application in solid state video cameras, analog delay lines, and linear signal processing is widespread. They rely, as we have seen, entirely on the fact that it takes a highquality MOS structure a very long time to reach equilibrium in inversion in the absence of any external source of the inversion layer carriers. Significantly, CCDs are very much a product of the integrated-circuit age, and they do not have a discrete-device analog, unlike most of the circuits we study in this text. CCDs were invented in 1972 and have frequently been touted as one of the few truly new device families since the dawn of the silicon revolution in the mid '60s.*

### 16.3 INVERTER SWITCHING TIMES AND GATE DELAYS

The problems of turning devices on and off and of estimating switching transients takes on practical significance in the world of digital logic and memory circuitry, where high computation speeds and short memory access times are major design objectives. As with many topics in this text, we can barely scratch the surface of this vast area, but we should be able to get at the essence of several important issues. We will first look at MOSFET logic and how the various, inverters we considered earlier compare. Then we will consider how TTL and ECL logic gate designs address the issue of speed. Finally we will look at issues that arise as we try to make devices and circuits smaller, in particular how MOSFET designs evolve through the process called scaling.

### 16.3.1 CMOS and Other MOSFET Inverters

We will begin our consideration of the speed of digital circuits with CMOS and then compare this logic family to other MOS logic families. Consider first the CMOS inverter circuit shown in Fig. 16.13a. We will take this circuit to represent a typical gate for purposes of calculating the switching transients. We make the following assumptions: First we assume that the input voltage changes from low to high, and vice versa, essentially instantaneously. We saw in Sec. 16.2.2 that we can turn a MOSFET on as fast as we want by making the source resistance sufficiently small, so for now we assume that this is not the dominant transient. Instead, we assume that the dominant switching transient is that associated with

[^32]

FIGURE 16.13
(a) CMOS inverter stage; (b) a plot of the current available for charging the output node as a function of the output voltage $v_{\text {OUT }}$; (c) a plot of the current available for discharging the output node as a function of $v_{\text {OUT }}$. The curves correspond to an inverter for which $V_{D D}=5 \mathrm{~V}, V_{T p}=-1 \mathrm{~V}, V_{T n}=1 \mathrm{~V}$, and $K_{n}=K_{p}=50 \mu \mathrm{~A} / \mathrm{V}^{2}$.
charging and discharging the load, which we take to be an ideal capacitor $C_{L}$. $C_{L}$ represents the loading presented by the inputs of the logic gates connected to the output node of the stage. Thus it is the fan-out of the stage times two-thirds the gate capacitance $C_{G}\left(=W L C_{o x}^{*}\right)$, plus any parasitic capacitance $C_{p}$ associated with the interconnecting loads. Assuming that the parasitic capacitance is small,* $C_{L}$ will be dominated by and proportional to $C_{G}$; that is,

$$
\begin{equation*}
C_{L}=n C_{G}+C_{P} \approx n C_{G} \tag{16.39}
\end{equation*}
$$

where $n$ is typically taken to be 3 or 4 . We will analyze a symmetrical CMOS gate with $V_{T n}=\left|V_{T p}\right|$ and $K_{n}=K_{p}$. Assuming that $C_{o x}^{*}$ is the same for both devices, and that $\mu_{e}=2 \mu_{h}$ and $L_{n}=L_{p}$, the condition that $K_{n}=K_{p}$ implies that we must have $W_{p}=2 W_{n}$.

Consider first the transient when the input goes from high to low. With the input high, the $n$-channel FET is on, the $p$-channel FET is off, and the output is zero, so $C_{L}$ is in its discharged state. When the input goes low, the $n$-channel
*It is not always a good assumption that $C_{p}$ will be small; see Sec. 16.3 .3 for more discussion of this topic.

FET turns off and the $p$-channel device turns on. In the steady state, the output voltage will be $V_{D D}$ and $C_{L}$ will be charged; thus

$$
\begin{equation*}
\Delta q_{\mathrm{A}}=C_{L} V_{D D} \tag{16.40}
\end{equation*}
$$

The charging current will be the drain current through the $p$-channel device when $v_{G S}$ is $-V_{D D}$; that is,

$$
i_{\mathrm{A}}= \begin{cases}\frac{K_{p}}{2}\left(-V_{D D}-V_{T p}\right)^{2}=\frac{K_{p}}{2}\left(V_{D D}-\left|V_{T p}\right|\right)^{2} & \text { for } v_{\mathrm{out}} \leq-V_{T p}  \tag{16.41}\\ K_{P}\left[-V_{D D}-V_{T p}-\frac{\left(v_{\mathrm{out}}-V_{D D}\right)}{2}\right]\left(v_{\mathrm{out}}-V_{D D}\right) & \text { for } v_{\mathrm{out}} \geq-V_{T p}\end{cases}
$$

The meaning of all of this is best seen by plotting $i_{\mathrm{A}}$ versus $v_{\text {OUT }}$, as is done in Fig. 16.13b. We see from this figure that the charging current remains large until $v_{\text {OUT }}$ is well over 3 V , after which it falls off approximately linearly to zero.

We have enough information to apply Eq. (16.9) and solve for the transient directly, but this is, frankly, too much work. For a first-order calculation, we do just as well to approximate $i_{\mathrm{A}}$ as a constant, $K_{p}\left(V_{D D}-\left|V_{T p}\right|\right)^{2} / 2$, during the entire transient and use Eq. (16.6). Doing this we find

$$
\begin{equation*}
\tau_{\mathrm{LO} \rightarrow \mathrm{HI}} \approx \frac{2 C_{L} V_{D D}}{K_{p}\left(V_{D D}-\left|V_{T p}\right|\right)^{2}} \tag{16.42}
\end{equation*}
$$

The transient when the input goes from low to high is very symmetrical. The $n$-channel device is now on, and the $p$-channel device is off, so the $C_{L}$ is discharged by the drain current of the $n$-channel device. This current is plotted as a function of $v_{\text {OUT }}$ in Fig. 16.13c. Again the prudent engineering choice is to approximate this current as constant over the transient at $K_{n}\left(V_{D D}-V_{T n}\right)^{2} / 2$, yielding

$$
\begin{equation*}
\tau_{\mathrm{HI} \rightarrow \mathrm{LO}} \approx \frac{2 C_{L} V_{D D}}{K_{n}\left(V_{D D}-V_{T n}\right)^{2}}=\tau_{\mathrm{LO} \rightarrow \mathrm{HI}} \tag{16.43}
\end{equation*}
$$

Equations (16.42) and (16.43) provide reasonable estimates of how quickly this CMOS inverter will switch, but even more importantly they also tell us how to design a faster inverter. That is, they teach us what the key parametric dependences are and where to direct our design efforts. Consider, for example, Eq. (16.43). We deduced earlier that $C_{L}$ was essentially $n C_{G}$ and that in CMOS gate $C_{G}$ is the sum of the gate capacitances of the $n$ - and $p$-channel MOSFETs. Thus

$$
\begin{equation*}
C_{L}=n\left(W_{n} L_{n}+W_{p} L_{p}\right) C_{\mathrm{ox}}^{*} \tag{16.44a}
\end{equation*}
$$

Since $W_{p}$ is $2 W_{n}$, this becomes

$$
\begin{equation*}
C_{L}=3 n W_{n} L_{\min } C_{\mathrm{ox}}^{*} \tag{16.44b}
\end{equation*}
$$

Using this in Eq. (16.42) yields

$$
\begin{equation*}
\tau_{\mathrm{LO} \rightarrow \mathrm{HI}}=\tau_{\mathrm{HI} \rightarrow \mathrm{LO}} \approx \frac{6 n W_{n} L_{\min }^{2} C_{\mathrm{ox}}^{*} V_{D D}}{W_{n} \mu_{e} C_{\mathrm{ox}}^{*}\left(V_{D D}-V_{T n}\right)^{2}}=\frac{6 n L_{\min }^{2} V_{D D}}{\mu_{e}\left(V_{D D}-V_{T n}\right)^{2}} \tag{16.45}
\end{equation*}
$$

Significantly, we see that the oxide capacitance and device width drop out of the picture. At the same time, the minimum gate length $L_{\min }$ enters quadratically, and we gain significantly if we can improve our technology and make $L_{\min }$ smaller. We also gain by keeping the threshold voltage near zero.

It would also seem that we should increase $V_{D D}$, since $\tau$ varies roughly as $\left(V_{D D}\right)^{-1}$, but we have to be careful about such a conclusion. We must realize that increasing $V_{D D}$ and reducing $L_{\min }$ impacts other important circuit characteristics, such as the power dissipation. For CMOS, the average power dissipation is given by Eq. (15.6) with $P_{\mathrm{ON}}$ and $P_{\mathrm{OFF}}$ equal to zero, and $E_{\text {CYCLE }}$ is given by $C_{L} V_{D D}^{2}$; thus

$$
\begin{equation*}
P_{\mathrm{AVE}}=f C_{L} V_{D D}^{2}=f 3 n W_{n} L_{\min } C_{\mathrm{ox}}^{*} V_{D D}^{2} \tag{16.46}
\end{equation*}
$$

The power-delay product PDP, which we defined in Sec. 15.1.3 to be $P_{\text {ave }} / f$, is thus

$$
\begin{equation*}
\mathrm{PDP}=3 n W_{n} L_{\min } C_{o \mathrm{x}}^{*} V_{D D}^{2} \tag{16.47}
\end{equation*}
$$



FIGURE 16.14
Currents available from the various MOS inverter stages to charge and discharge a load: (a) a resistor load or an enhancement mode load biased in its linear region; ( $b$ ) a depletion mode load (i.e., $n$-MOS); (c) CMOS. In all cases the $n$-channel enhancement mode device is assumed to have $K=40 \mu \mathrm{~A} / \mathrm{V}^{2}$ and $V_{T}=1.5 \mathrm{~V}$. The resistor load is $40 \mathrm{k} \Omega$. The $n-\mathrm{MOS}$ depletion mode load has $K=250 \mu \mathrm{~A} / \mathrm{V}^{2}$ and $V_{T}=-1 \mathrm{~V}$, and the CMOS $p$-channel device has $K=40 \mu \mathrm{~A} / \mathrm{V}^{2}$ and $V_{T}=-1.5 \mathrm{~V}$.

Now we can see that it is important to reduce $W_{n}$ and $C_{o x}^{*}$, along with $L_{\text {min }}$, and that although increasing $V_{D D}$ may reduce the switching time, the power goes up faster than the delay comes down. The better direction to go is toward reducing $V_{D D}$. We will have more to say about these issues in Sec. 16.3.3.

CMOS is the lowest-power MOS logic because it dissipates power only during switching, but it is not necessarily the fastest because $C_{L}$ is relatively large (i.e., we have to turn on two MOSFETs per inverter, one with twice the gate area of the other). In Chap. 15 we discussed four other MOSFET logic families, each of which used a different load device; we had resistor load, saturated enhancement mode load, linear enhancement mode load, and depletion mode load ( $n$-MOS). In terms of the $\tau_{\mathrm{LO} \rightarrow \mathrm{HI}}$ transient, $C_{L}$ will be charged by the drain current of the load device, so the larger this current is, the shorter the transient. This current is plotted versus vout for several of the loads in Fig. 16.14, assuming the same static power dissipation in each inverter. (We also assume that each circuit uses the same driver, so that $C_{L}$ is the same for each.) The depletion mode load (i.e., $n$ MOS) has the shortest transient of those shown because it maintains the charging current higher over more of the transient.

In terms of the discharge transient $\tau_{\mathrm{HI} \rightarrow \mathrm{LO}}$, the current discharging $C_{L}$ is the drain current of the driver device minus the load device current. This is also shown in Fig. 16.14. (Note that $v_{\text {OUT }}$ does not become zero with the loads illustrated in parts $a$ and $b$.) From this figure we see that those circuits with the larger charging currents through the load have correspondingly smaller discharging currents and that $n$-MOS is actually the slowest during this portion of the transient. However, if we consider a full cycle, which involves both transients, $n$-MOS is fastest overall because with it both currents are maintained high over the largest portions of the transients.

To quantify the $n$-MOS transients we assume that the charging current is constant over the entire transient and is equal to $K_{D} V_{T D}^{2} / 2$, where $K_{D}$ and $V_{T D}$ are the $K$-factor and the threshold, respectively, of the depletion mode load device. Similarly, the discharging current is $\left[K_{E}\left(V_{D D}-V_{T E}\right)^{2}-K_{D} V_{T D}^{2}\right] / 2$, where $K_{E}$ and $V_{T E}$ pertain to the enhancement mode driver device. Thus we have

$$
\begin{gather*}
\tau_{\mathrm{HI} \rightarrow \mathrm{LO}}=\frac{2 C_{L} V_{D D}}{K_{D} V_{T D}^{2}}  \tag{16.48}\\
\tau_{\mathrm{LO} \rightarrow \mathrm{HI}}=\frac{2 C_{L} V_{D D}}{K_{E}\left(V_{D D}-V_{T E}\right)^{2}-K_{D} V_{T D}^{2}} \tag{16.49}
\end{gather*}
$$

For a given $K_{E}$, the sum of these two times will be minimized when $K_{D} V_{T D}^{2}=$ $K_{E}\left(V_{D D}-V_{T E}\right)^{2} / 2$, in which case we have

$$
\begin{equation*}
\tau_{\mathrm{HI} \rightarrow \mathrm{LO}}=\tau_{\mathrm{LO} \rightarrow \mathrm{HI}}=\frac{4 C_{L} V_{D D}}{K_{E}\left(V_{D D}-V_{T E}\right)^{2}} \tag{16.50}
\end{equation*}
$$

$C_{L}$ will be approximately $n W_{E} L_{E} C_{\mathrm{ox}}^{*}$, and $K_{E}$ is $\mu_{e} W_{E} C_{\mathrm{ox}}^{*} / L_{E}$, so with $L_{E}=$ $L_{\text {min }}$ this becomes

$$
\begin{equation*}
\tau_{\mathrm{LO} \rightarrow \mathrm{HI}}=\tau_{\mathrm{LO} \rightarrow \mathrm{HI}}=\frac{4 n L_{\min }^{2} V_{D D}}{\mu_{e}\left(V_{D D}-V_{T E}\right)^{2}} \tag{16.51}
\end{equation*}
$$

Comparing this result to Eq. (16.45), we see that the $n$-MOS is somewhat faster. However, it is important to also realize that $n$-MOS's advantage is not large, and that this advantage will be reduced if the parasitic interconnect capacitance is significant because the currents are larger in CMOS, all else being equal.

A final observation concerning $n$-MOS is that the switching power is also less than in CMOS, again because $C_{L}$ is smaller, so when operating at top speed, $n$-MOS will dissipate less power. Unfortunately, many gates in a complex logic circuit or a static memory do not switch rapidly but instead sit and wait. In that case the real advantage is in having a low static power dissipation, for which CMOS is far superior.

### 16.3.2 TTL and ECL Gates

The excess carrier charge stores in a bipolar transistor are intrinsic to the operation of this device and are directly proportional to the junction currents. As we saw in Sec. 16.2.1b, the charging and discharging rates of these stores are not changed by increasing the operating current levels of a given device. At the same time, however, there are parasitic charge stores associated with any logic gate circuit, and the delays involved with charging and discharging these stores will definitely decrease as the operating currents are increased. The idea then in operating bipolar logic to achieve the shortest switching transients is to operate at a high enough high current level that the intrinsic switching delays due to the excess charge stores are the dominant delays. There is no point in increasing the currents beyond the level where this occurs because the switching delays cannot be reduced further.

As the currents are increased the power dissipation will also increase. Initially, as the switching delays are decreasing, this is just the classic trade-off between speed and power. Ultimately, however, the switching delay saturates at some minimum bound, the intrinsic switching delay, and further increases in current just lead to more power dissipation without a corresponding increase in speed.*

The two bipolar logic families we discussed in Chap. 15, transistor-transistor logic (TTL) and emitter-coupled logic (ECL), each take a different approach to the problem of achieving switching speeds limited only by intrinsic time constants. We will take a brief qualitative look at each now.
a) TTL. A basic transistor-transistor gate, which we discussed in Sec. 15.3.2, is illustrated in Fig. 16.15. The first thing to recall is that TTL is a saturating logic family, meaning that some of the bipolar transistors in the circuit, specifically $Q_{D}$ and $Q_{S}$, are in saturation when the input is high. We saw earlier that with a
*There is no corresponding delay saturation in MOSFETs; a MOSFET always switches faster with a larger input current. The problem with MOSFETs is getting large currents from them, which is why we try to make them smaller. The problems involved with this are discussed in Sec, 16.3.3.


FIGURE 16.15
Transistor-transistor logic inverter stage similar to that discussed in Sec. 15.3.2 and illustrated in Fig. 15.16.
constant base current we can turn a BJT on and drive it into saturation faster than we can bias it into the forward active region. The transient is even faster if we put a Schottky diode in parallel with the critical base-collector junctions (i.e., by using Schottky clamps), and this is common practice in TTL.

Looking at the TTL gate, we see that large base currents are supplied to turn on and saturate $Q_{D}$ and $Q_{S}$ when the inputs are high. The turn-on transient will thus be relatively fast.

To turn a TTL gate off, the excess charge stored in the bases of $Q_{D}$ and $Q_{S}$ has to be removed. $Q_{B}$ plays an important role in this because it becomes active and can actually pull a larger current out of the base of $Q_{D}$ than the original charging current. Once $Q_{D}$ is off and its collector current has become small, $Q_{S}$ will begin to turn off. There is no device actively removing charge from the base of $Q_{S}$, but it can discharge through $R_{E}$. Furthermore, as the collector current continues to flow it will itself discharge the excess carrier charge store in the base. The key step, clearly, is turning $Q_{D}$ off so that the process of discharging $Q_{S}$ can begin, and $Q_{B}$ does this very effectively.

The transistor $Q_{L}$ is important in providing drive to charge any parasitic charge stores associated with the output node. As we mentioned in Chap. 15, this active element is much more effective than a collector resistor in providing the necessary charging current. In the other half of the transient, when the output node must be discharged, $Q_{S}$ is active and will quickly draw charge off the output node.

Summarizing TTL, we see that it is a so-called saturating logic that uses Schottky clamping to keep the key transistors from actually saturating and uses
several active transistors (i.e., $Q_{B}, Q_{L}$, and $Q_{S}$ ) to charge and discharge key charge stores in the gate.
b) ECL. A basic emitter-coupled logic gate, which we first discussed in Sec. 15.3.3, is illustrated in Fig. 16.16a. Unlike TTL, ECL is a nonsaturating logic family; during switching the transistors in the circuit are changed between bias points in cutoff and the forward active region. This is illustrated in Figs. 16.16b


FIGURE 16.16
(a) Emitter-coupled logic inverter stage similar to that discussed in Sec. 15.3.3 and illustrated in Fig. 15.17; (b) the voltage and current levels in a representative stage when the input is low; (c) the voltage and current levels when the input is high.
and $c$, in which the voltage and current levels are indicated on a representative ECL gate (the one used in the example on page 533) with the input, respectively, low and high.

Figures $16.16 b$ and $c$ can also help us understand the switching transients in an ECL gate. Imagine first that the input, after having been low, is suddenly changed to high (i.e., 4.4 V ). Since the emitter of $Q_{1}$ is initially at 3.4 V , the bias on the base-emitter junction is actually quite large and a relatively large base current will flow, helping to turn on $Q_{1}$ quickly. As $Q_{1}$ turns on, however, the current through $R_{3}$ increases, raising the voltage on the emitter nodes of $Q_{1}$ and $Q_{2}$. This causes $Q_{2}$ to turn off, and the current shifts from $Q_{2}$ to $Q_{1}$, as we want. It also reduces the forward base-emitter bias on $Q_{1}$, reducing the base current and ensuring that $Q_{1}$ will not be driven into saturation. Thus the base current of $Q_{1}$ is high initially when we need it and then falls off.

Next consider the transient as the input of $Q_{1}$ is made low, after having been high. Now the emitter-base bias on $Q_{1}$ is actually negative initially, which helps discharge the base, but the main factor discharging the base is the collector current. As $Q_{1}$ turns off, the voltage on the emitter falls as the voltage across $R_{3}$ decreases. This in turn increases the bias on $Q_{2}$, turning it on more quickly, much as $Q_{1}$ was turned on during the other transient.

Another important aspect of ECL is the reduced role played by parasitic charge stores in the circuit. The role is reduced by two factors. First, the voltage swings in ECL are much less than in the other logic families we have studied. The sizes of the charge stores are correspondingly smaller. Second, ECL operates at relatively high current levels, meaning that there is more current available to charge and discharge the parasitic charge stores. The downside of ECL is that it dissipates a lot of power, but it is the fastest logic family.

### 16.3.3 Device and Circuit Scaling

It is clear from our preceding discussions that making devices smaller makes them and the switching circuits that incorporate them faster. Thus it is a general objective of device and circuit designers as well as process engineers to be able to reduce the size of devices. At the same time, however, we recognize that there are complex interactions between the device parameters and the performance of even a simple inverter and that we must be careful to understand the full impact of any changes made. To explore this point further, we will look now at the complications involved in reducing the size of a MOSFET circuit.

We mentioned in Sec. 16.3.1 that reducing the channel length and supply voltage improves the speed and power performance of a MOSFET inverter. As we make these changes, however, we also have to adjust other parameters such as the gate width and threshold voltage, so that we maintain the proper transfer characteristic for maximum noise margins and optimum trigger voltage. Concerns such as this have led to the development of rules to follow when reducing the dimensions and operating levels of a logic family. This process is called scaling, and the rules are called scaling rules. The use of the verb scale in this context
implies that it is necessary to somehow shrink the inverter dimensions and its operating parameters in unison to ensure proper operation.

To explore this issue a bit more, imagine that we have made advances in our processing technology and we are now able to reduce the gate length of our MOSFETs by a factor $s$ from $L$ to $L / s$, where $s>1$. We call $s$ our scaling factor. If we reduce $L$, we should also reduce the gate width $W$ by the same factor to $W / s$, so that $K$ and our transfer characteristics stay the same. If these two dimensions are all that we change, none of the device terminal characteristics change, but the power and switching delay both decrease [see Eqs. (16.45) and (16.46)]. It sounds like a big win all around.

There are subtleties that arise, however, that complicate this picture. Very importantly, as we reduce the lateral dimensions of a MOSFET we find that we must also reduce the vertical dimensions to keep the device operating as much as possible in the gradual channel approximation regime (i.e., in such a way that the drift fields and currents in the channel are predominantly parallel to the gate- $y$-directed in our convention). This may sound like a strange constraint because, although we have seen that the gradual channel approximation is a very convenient model, it is hard to justify restricting a device's structure just for our convenience! Of course, we can't justify such constraints on this basis; the real reason we try to design a device to operate in this regime is because that is where we find we obtain the optimal device characteristics. That is, we find in practice that unless we scale a device's dimensions vertically, as well as horizontally, the device characteristics are severely degraded. Specifically, we find that the output conductance $g_{o}$ increases and that it may even be impossible to turn the device off (i.e., to close the switch, as it were). Thus the reason we also scale vertically is to get good output characteristics.

To scale vertically by a scaling factor $s$, we must increase the substrate doping as $s^{2}$ to decrease the depletion region width as $1 / s$, and we must scale the oxide thickness by $1 / s$, which increases $C_{o x}^{*}$ by $s$. The net effect on $K$ of these changes is to increase it by $s$, which means the currents in the circuit will be larger by a factor of $s$ if we operate at the same voltages.

Changes in both the oxide thickness and the substrate doping level combine to reduce the magnitude of several terms in the threshold voltage $V_{T}$ by $1 / s$, although other terms are unaffected. Through processing, we can choose to compensate for these changes to keep $V_{T}$ unchanged or we can scale $V_{T}$ by $1 / s$. Our decision depends on what we do with the supply voltage $V_{D D}$.

If we scale both the power supply and threshold voltages by a factor of $1 / s$, the drain currents in the circuit will also scale as $1 / s$ because they are proportional to these voltages squared, a factor that scales as $1 / s^{2}$, and to $K$, which scales as $s$. For a fixed operating frequency $f$, the gate delay will then scale by $1 / s$ [see Eq. (16.45)], and the dynamic power dissipation per gate will scale as $1 / s^{3}$. The tendency will be to increase $f$ proportionally to the decrease in gate delay, however, since we always want things to go faster, and if we scale $f$ by $s$ the dynamic power dissipation per gate will scale as $1 / s^{2}$, since it is proportional to $f$. These effects are summarized in Table 16.1.

Table 16.1

|  |  | Scaling factors for operating voltage scaling factor of $1 / \mathrm{s}$ |  | Scaling factors for operating voltage scaling factor of 1 |  |
| :---: | :---: | :---: | :---: | :---: | :---: |
| Drain current Gate delay |  | $\begin{aligned} & 1 / s \\ & 1 / s \end{aligned}$ |  | 1. |  |
|  |  | Frequency scaling factor |  | Frequency scaling factor |  |
|  |  | 1 | $s$ | 1 | $s$ |
| Dynamic power | Per gate | $1 / s^{3} \quad 1 / s^{2}$ |  | 1/s |  |
|  | Per $\mathrm{cm}^{2}$ | 1/s |  | $s^{2}$ |  |
| Statics power | Per gate | $1 / s^{2}$ | $1 / s^{2}$ | $s \quad s$ |  |
|  | Per $\mathrm{cm}^{2}$ | $1 \quad 1$ |  | $s^{3} \quad s^{3}$ |  |
| Current density in metal |  | Metal and field oxide thickness scaling factor |  | Metal and field oxide thickness scaling factor |  |
|  |  | 1/s | 1 | 1/s | 1 |
|  |  | $s \quad 1$ |  | $s^{3} \quad s^{2}$ |  |
| Charging time | Scaled length | 1/s | $1 / s^{2}$ | $1 / s^{2}$ | $1 / s^{3}$ |
|  | Fixed length |  | 1/s | 1/s | $1 / s^{2}$ |

The static power dissipation per gate in $n$-MOS and the other MOSFET families in which it is relevant scales as $1 / s^{2}$ also. This comes about because the static power is proportional to the product of $V_{D D}$ and $I_{\mathrm{ON}}$, both of which scale as $1 / s$.

Notice, finally, that the area occupied by a given circuit will scale as $1 / s^{2}$ if we scale all of the lateral dimensions by $1 / s$, and thus the power dissipation per square centimeter in an integrated circuit will stay constant since power and area both scale by $1 / s^{2}$. This is fortunate because if the power did not go down at least as fast as the area of the circuit, the power density would increase and limit how tightly circuits could be packed on an integrated-circuit chip. With a constant power dissipation density, the number of circuits that can be placed on a given size chip scales (increases) as $s^{2}$, a very significant factor.

Clearly it is desirable to scale the supply voltage, $V_{D D}$, but we must also be aware of the realities and restrictions of the marketplace. Many circuits are designed to replace existing circuits already in use in systems, and many others are designed to be compatible with existing integrated-circuit product lines. In both cases, the power supply voltages are fixed and the designer does not have the freedom to change them. On the other hand, the practical incentives to develop new
generations of circuits and systems that operate on lower supply voltages is clearly strong, and "standard" supply levels have decreased over the years from 12 V to 9 V to 5 V to, more recently, 3 V . Scattered circuits biased from $2-\mathrm{V}$ and even $1-\mathrm{V}$ supplies are even found. (The $1-\mathrm{V}$ increments seen at the lower voltage levels correspond to the nominal voltage available from most dry battery cells.)

Also in scaling voltages, we must be aware of the realities of circuit operation in a real, noisy environment. If we scale the voltages as $1 / s$, then the high and low voltage levels and the noise margins will all be scaled by $1 / s$. If we scale far enough (i.e., make $s$ large enough), the noise margins will become impractically small and the circuit will no longer operate reliably. There is thus a very real limit to how far we can scale a given design.

If for whatever reason we cannot reduce the voltages in a circuit as we scale the dimensions, we run the risk of exceeding breakdown fields at certain critical points, especially in the gate regions. Electric field is voltage divided by length, and thus if the voltages are unchanged and dimensions are scaled by $1 / s$, the field strengths will scale as $s$. Only by also scaling voltages by $1 / s$ can we keep the electric field strengths from increasing dangerously.

Another consequence of not scaling the voltage is that the dissipated power density increases dramatically. The currents now scale as $s$, rather than as $1 / s$, and if the frequency is increased as $s$, the dynamic power density increases as $s^{2}$ ! Clearly we cannot increase the packing density very much at this rate before we get into trouble with excessive heating.

Finally, consider what is happening in the thin film interconnects (i.e., wires) in an integrated circuit and with the parasitic elements as we scale. The currents are scaled as $1 / s$, as we have said. Because we assume that we scale both the thickness and the width of the interconnect lines, the conductor cross-sectional area is scaled as $1 / s^{2}$. The current densities in these conductors thus scale as $s$ (i.e., they increase). This can lead to serious reliability problems because the metal can actually be moved at very high current densities, a phenomenon called electromigration, and this is to be avoided. Consequently, the thicknesses of the metal films used as interconnects on an integrated circuit are usually not scaled, so the cross-sectional area of the leads scales more nearly as $1 / s$ and the current density stays constant.

Parasitic lead capacitances should scale roughly as $1 / s$, because lateral areas scale as $1 / s^{2}$ and capacitances per unit area scale as $s$ (the vertical thickness scales as $1 / s$ ). Lead resistances will scale as 1 if the metal thickness is not scaled and as $s$ if it is. In the former case, any relevant RC time constants scale as $1 / s$, a desirable result, whereas in the latter case they are unchanged.

The impact of scaling on the time required to charge a parasitic capacitance with a current-source-like input will depend on whether or not the voltages are scaled. To see this we begin with Eq. (16.6) and rewrite $\Delta q_{\mathrm{A}}$ as $C_{\mathrm{A}} \Delta v_{\mathrm{AB}}$, where $C_{\mathrm{A}}$ is the parasitic capacitance; this yields

$$
\begin{equation*}
\tau_{T}=\frac{C_{\mathrm{A}} \Delta v_{\mathrm{AB}}}{\bar{I}_{\mathrm{A}}} \tag{16.52}
\end{equation*}
$$

Writing the transient time in this way, we can see that if the voltages as well as dimensions are scaled, then $\tau_{T}$ will decrease as $1 / s$ because $C_{\mathrm{A}}, \Delta \nu_{\mathrm{AB}}$, and $\bar{I}_{\mathrm{A}}$ all scale as $1 / s$. If the voltages are not scaled, then $\tau_{T}$ decreases even more quickly (i.e., as $1 / s^{2}$ ) since the charging current $\bar{I}_{\mathrm{A}}$ is now larger by a factor of $s$, whereas $C_{A}$ is smaller by $1 / s$ and $\Delta v_{A B}$ is unchanged.

The preceding discussion assumes that the capacitances scale as $1 / s$ because we have assumed that all of the dimensions are scaled as $1 / s$. We have seen in the case of metal interconnects, however, that there are good reasons not to scale all of the vertical dimensions in an integrated circuit; that is, we are better off keeping the metal lines thicker. The same is true of the dielectric layers other than the dielectric under the MOSFET gate. If we do not scale the dielectric layers in the so-called field regions (i.e., in the regions outside of the gate regions) but instead keep them thick, then the parasitic capacitances associated with them will scale as $1 / s^{2}$ rather than simply as $1 / s$ and the delay times associated with charging or discharging these parasitic charge stores will be correspondingly smaller, scaling as $1 / s^{2}$ if the voltages are scaled and as $1 / s^{3}$ if they are not.

Any RC time constants associated with metal leads also decrease if the field dielectric is not scaled; in fact, they decrease by as much as $1 / s^{2}$ if both the metal and field dielectric are kept thick (i.e., are not scaled).

This all sounds pretty good, but there is one important further consideration. As we scale circuits and increase their density we are not content only to make smaller versions of the same circuits; instead we tend to want to make larger and larger circuits. An obvious example is a memory array. We don't want smaller 1-Mbit chips; we want to replace our 1-Mbit chips with 4-Mbit chips that fit the same package. The result is that the length of critical path interconnect lines often does not decrease at all, (i.e., it scales as 1 rather than as $1 / s$ ). The corresponding parasitic capacitances then scale only as $1 / s$, assuming the field dielectric is kept thick (not scaled), and the transient associated with charging the parasitic capacitance of a line with a current source [e.g., Eq. (16.52)] scales as $1 / s$ (i.e., decreases).

The overall picture we have presented of the problem of scaling a MOSFET inverter circuit is summarized in Table 16.1. To summarize its message and our discussion in a general way, we can say that we have seen that making devices smaller is important to making circuits faster and to reducing power dissipation, but we have also seen that any changes must be made in concert. We have seen that certain parameters, such as the thickness of the interconnect metal and of the field dielectric, are best left unchanged, whereas other parameters, such as the power supply voltages and the size of the chip, may be dictated by other considerations.

There are several other interesting things to note specifically in looking at Table 16.1. First, it is clear from the right-hand columns that not scaling the voltages actually makes a circuit faster, as we have noted before, but it also results in rapid increases in the power densities. This is particularly true of the static power and is another strong argument for CMOS. Not scaling the voltages also has a major negative impact on the current densities in the metal lines,
even if the metal thickness is not scaled. It is clear from the table that we must eventually face the need to scale operating voltages to keep the power and current densities under control. It is also clear that we must not scale the metal and field oxide thickness if we want to increase the operating frequency of the circuit. This requires that the charging time (the last line in Table 16.1, assuming that we also want to keep the chip size large and pack more circuitry onto it) scale at least as $1 / s$, and this occurs only in the second column for a situation in which the voltage is also being scaled, as we have urged we should try to do. Finally, we should point out that we have assumed that all dimensions and voltages are being scaled by the same amount. Although it is desirable to scale the dimensions by the same factor, a different factor could be used for the voltages as a compromise between the demands of increasing the operating speed, keeping the power and current densities under control, and fitting in with existing voltage level standards and convention.

### 16.4 SUMMARY

In this chapter we have considered the problem of estimating the large-signal switching times of nonlinear semiconductor devices. We have seen that charge stores, which are also often nonlinear, in devices and circuits are the primary limitations to how quickly the state of a device or circuit can be changed.

We have looked at the general problem of switching and have identified two situations in which it is possible to obtain reasonable, perhaps even analytical, solutions. One such situation occurs when the current charging or discharging a charge store can be approximated by a constant value over the duration of the transient. In that case the transient time is approximately just the total charge store divided by the current [Eq. (16.6)]. The second situation we identified occurs when the charge store can be approximated as a fixed-value linear capacitor over the duration of the transient. In this case, the time derivative of the voltage is directly proportional to the current [Eq. (16.9)] and the transient waveform is found by integrating the current.

We have also looked at the specific problems of turning devices on and off and have turned to using this information to estimate the switching times of digital circuits. We have seen that bipolar junction devices, specifically $p-n$ diodes and BJTs, have intrinsic diffusive charge stores that are directly proportional to terminal currents. This then places a lower limit on the switching time that is essentially independent of the operating current level, assuming that we are at current levels sufficiently large that the parasitic charge stores are negligible. MOSFETs, on the other hand, can be turned on or off arbitrarily quickly if a large enough current is supplied to charge or discharge the gate (until, of course, the switching times approach the transit time of carriers through the channel); the real problem is getting enough current from a MOSFET to switch the following device quickly. In this light, we have looked at the implications of making devices smaller and the options we face in doing so. We have used MOSFET logic as the vehicle to examine scaling rules and have shown that it is desirable to scale the
device dimensions and the operating voltages as much as possible while keeping the metal and field oxide thicknesses unchanged. This allows us to realize the attractive goals of increasing the operating frequency, maintaining the same chip size, and not melting the circuit.

## PROBLEMS

16.1 Three possible connections of a bipolar transistor as a diode were illustrated in Fig. 16.3. To quantify the differences in the switching behaviors of those connections, consider using a transistor with $w_{E}=2 w_{B}=0.2 w_{C}=1 \mu \mathrm{~m}, N_{D E}=$ $5 N_{A B}, N_{A B}=5 N_{D C}$, and $N_{A B}=5 \times 10^{16} \mathrm{~cm}^{-3}$. Assume that the minority carrier lifetimes are infinite and that $D_{e}=3 D_{h}=30 \mathrm{~cm}^{2}$; s throughout the device.
(a) Sketch the excess minority carrier populations in the transistor for each of the connections, assuming a moderate forward bias, (i.e., $V_{D} \gg k T / q$ ). Notice that in the connection of Fig. $16.3 b$ the base-collector junction actually becomes forward-biased.
(b) Estimate the duration of the first portion of the switching transient, $\tau_{1}$, and the time constant in the second portion, $\tau_{2}$ (refer to Figure 16.2) in the connection of Fig. 16.13a.
(c) Repeat part $b$ for the connection of Fig. 16.3c.
(d) Now consider the connection in Fig. 16.3b.
(i) What happens to the excess carriers stored in the collector region as the transistor is turned off; that is, how does the excess dissipate?
(ii) Based on your understanding of (i), how would you expect the turn-off transient in this connection to compare to those of the connections Figs. $16.3 a$ and $c$ ?
16.2 You are asked to estimate the switching speed of the chain of bipolar inverters described in problem 15.11. Follow the steps outlined below:
(a) Sketch the excess minority carrier charge distribution in one transistor of the inverter chain when that transistor is on and its output is low. Label the vertical axis (i.e., $p^{\prime}$ and $n^{\prime}$ ) in terms of the current-source value $I$ and the device parameters specified in the problem statement (algebraic expressions are expected).
(b) Estimate the time for a transistor in this inverter to turn on when its input voltage is suddenly changed from $V_{\mathrm{LO}}$ to $V_{\mathrm{HI}}$; give your answer in terms of the current $I$ and the parameters given.
(c) Estimate how many times faster or slower the same transistor turns off when the output of the preceding stage switches suddenly from high to low (i.e., from $V_{\mathrm{HI}}$ to $V_{\mathrm{LO}}$ ).
16.3 In Sec. 16.2.1a, we considered turning a diode on (and off) when it was connected through a resistor to a voltage source. Now consider turning a diode on with a current source, as illustrated in Fig. P16.3.
Assume that you have a silicon $p^{+}-n$ diode with $w_{p}=w_{n}=10 \mu \mathrm{~m}, D_{e}=$ $40 \mathrm{~cm}^{2} / \mathrm{s}, D_{h}=15 \mathrm{~cm}^{2} / \mathrm{s}, N_{A p}=5 \times 10^{18} \mathrm{~cm}^{-3}, N_{D n}=5 \times 10^{16} \mathrm{~cm}^{-3}$, and $\tau_{\min }=\infty$. The cross-sectional area of the device is $10^{-4} \mathrm{~cm}^{2}$, and $I_{T}$ is 1 mA .
(a) Draw the excess carrier population distributions in this device for $t \gg 0$.
(b) Calculate the turn-on transient time of this device assuming the dominant charge store is that in the excess carrier populations.


FIGURE P16.3
A p-n diode driven by a current source (above, left). In this problem the current source varies with time as illustrated on the right.
(c) What is $v_{\mathrm{AB}}$ for $t \gg 0$ ?
(d) Sketch (qualitatively) the excess carrier population profile in this device at several times during the transient to illustrate how it will evolve with time.
(e) Your sketches for part $d$ should show $p^{\prime}\left(0^{+}\right)$increasing with time. What will be the approximate function dependence of $p^{\prime}\left(0^{+}\right)$on time?
$(f)$ How do you expect $v_{\mathrm{AB}}$ to depend on time for $t \geq 0$ ?
(g) Calculate the change in charge stored in the junction depletion regions, and estimate how much time supplying this charge adds to the transient.
16.4 Problem 16.3 concerned turning a diode on with a current source. In this problem we consider turning the same diode off with a current source. The circuit is the same as in problem 16.3 , but now consider the current waveform shown in Fig. P16.4. After the current changes sign at $t=0$, reverse current $I_{T}$ flows through the diode. Initially this current primarily removes charge from the diffusion charge store (i.e., excess carriers). After $v_{\mathrm{AB}}$ reaches zero and becomes negative, this current charges the junction depletion region. This continues until $v_{A B}$ is sufficiently negative that the junction breaks down, at which point the transient is complete.
(a) Estimate the time at which $\nu_{\mathrm{AB}}=0$; call this $\tau_{R 1}$.


FIGURE P16.4
(b) Assuming that once $v_{\mathrm{AB}}$ is zero all of the current contributes to building the depletion region, how long does it take after $\tau_{R 1}$ for the junction to breakdown if the breakdown field is $3 \times 10^{5} \mathrm{~V} / \mathrm{cm}$ ? Call this time $\tau_{R 2}$.
(c) How does $\nu_{\mathrm{AB}}$ vary with time for $\tau_{R 1} \leq \tau \leq \tau_{R 2}$ ?
(d) What is $v_{\mathrm{AB}}$ at $t=\tau_{R 2}$ ?
16.5 Consider an abrupt $p-n$ diode with $w_{n}=w_{p}=2 \mu \mathrm{~m}, N_{A p}=10^{17} \mathrm{~cm}^{-3}, N_{D n}=$ $5 \times 10^{18} \mathrm{~cm}^{-3}$, and $\mu_{e}=4 \mu_{h}=1600 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}$. Assume also that the minority carrier lifetime is infinite.
(a) What is the ratio of hole to electron current across this junction? Are you justified in neglecting one of these current components?
(b) What is $\tau_{\mathrm{tr}}$ for this device? [See Eq. (16.16).]
(c) How does $\tau_{\mathrm{tr}}$ change if $w_{n}$ and $w_{p}$ are reduced to $0.5 \mu \mathrm{~m}$ ?
(d) If the original diode had been symmetrically doped with $N_{D n}=N_{A p}=$ $10^{17} \mathrm{~cm}^{-3}$, what would $\tau_{T}$ in Eq. (16.13) be? To answer this, first derive the general expression for $\tau_{T}$ in a symmetrically doped diode. State your result, and then evaluate it for this specific device.
(e) What is the ratio of hole to electron current in the diode of part d ? Comment on this result in light of your answer in part d .
16.6 (a) Calculate the emitter, base, and collector transit times for the transistor structure described in problem 8.1.
(b) Calculate the same quantities you did in part a for a pnp transistor in which the magnitudes of the doping levels in the emitter, base, and collector are identical to those in the $n p n$ device. Assume $\mu_{e}=2.5 \mu_{h}$.
(c) Comment on the relative speed of $n p n$ and $p n p$ bipolar junction transistors. Consider both turn-on and turn-off transients.
16.7 (a) The analysis of the transients when driving a transistor into and out of saturation in Sec. 16.2.1b assumed that $R_{S}$ and $R_{C}$ in Fig. 16.4 were equal. Establish the duration of the turn-on transient if you instead have $R_{S}=5 R_{C}$. (Continue to use $V_{S}=V_{C C}$.)
(b) Discuss the effect of changing $R_{S}$ from $R_{C}$ to $5 R_{C}$ on the turn-off transient, that is, when the switch in Fig. 16.4 is changed from the middle to the upper position.
16.8 (a) In the discussion of the turn-on transient of a MOSFET in Sec. 16.2.2a, the gate was precharged to a voltage $V_{T}$ and the MOSFET was always on. Consider now how the turn-on transient would differ if this had not been done, that is, if the $V_{T}$ source in Fig. 16.7 were not there and the switch made connection to ground in the lower position.
(b) Derive an expression for the duration of the initial portion of the transient (i.e., the time for $v_{G S}$ to change from 0 to $V_{T}$ ). Evaluate your result if $V_{S}=5 \mathrm{~V}, V_{T}=$ 1 V , and $R_{S} C_{G}=10^{-8} \mathrm{~s}$.
16.9 Immediately after turning on, the MOSFET in the circuit in Fig. 16.7 is in saturation, and it stays in saturation until $v_{\text {OUT }}(t)=v_{G S}(t)-V_{T}$. Until we know what type of capacitive loading is connected to the output terminal we cannot calculate $\nu_{\text {OUT }}(t)$, so it is not possible to calculate how long the MOSFET remains saturated [where Eq. (16.29) is valid] and when it becomes linear (at which point the capacitance of the gate increases and the gate-to-drain capacitance assumes a nonzero value). We can, however, set bounds on this $v_{G S}$ and thus bound the duration of the saturated portion of the transient. In working this problem use $R_{S} C_{G}=10^{-8} \mathrm{~s}$.
(a) The minimum bound will occur if there is no capacitive loading of the output, in which case $v_{\text {OUT }}(t)$ responds instantly to $v_{G S}(t)$. Derive an expression for the value of $v_{G S}$ at which $v_{\text {OUT }}=v_{G S}-V_{T}$, and use your result to find an expression for the minimum length of the time the transistor can be in saturation. Evaluate your result assuming $V_{S}=5 \mathrm{~V}, V_{T}=1 \mathrm{~V}$, and $R_{D} K=2 \mathrm{~V}^{-1}$.
(b) The maximum bound on the transient will occur when there is so much capacitive loading that $V_{\text {out }}(t)$ doesn't change during the transient (i.e., remains at $V_{S}$ ). If this is the case, at what value of $v_{G S}$ does the transistor go out of saturation? Can you suggest an algorithm for defining the duration of the transient in this situation? Use your answer to calculate a time.
16.10 Consider a DRAM cell like that illustrated in Fig. 15.20.
(a) Estimate the storage time of a cell with the following parameters:

| Diode current | As in Fig. 7.8 |
| :--- | :--- |
| $n^{+}-p$ junction area | $5 \mu \mathrm{~m} \times 5 \mu \mathrm{~m}$ |
| Capacitor area | $10 \mu \mathrm{~m} \times 10 \mu \mathrm{~m}$ |
| Oxide thickness | 30 nm |
| Supply voltage $V_{D D}$ | 5 V |
| MOS thresholds $V_{T}$ | 1 V |

(b) The time you found in part a should have been rather substantial, and actual RAM storage times are much shorter because of additional leakage paths. One such path corresponds to excess diode current around the perimeter of the junction at the oxide interface. How will your answer change if there is an additional current of $10^{-10}$ A per centimeter of perimeter?
(c) Another source of leakage is subthreshold conduction, which is current flow between the source and drain of a MOSFET that occurs even though the device is cutoff. (We modeled this as $R_{S D}$ in Fig. 10.9.) Suppose that this current is $10^{-8}$ A per centimeter of gate width and that the gate is $5 \mu \mathrm{~m}$ wide. What is the storage time now?
16.11 A determining factor in the speed of a charge-coupled device is the time required to transfer the charge from one gate to the next, as shown in Fig. 16.10c. We can get a rough estimate of how long this is by assuming that the electrons in the charge packet move by drift and that the drift field is the voltage difference between the electrodes, $V_{\mathrm{Tr}}-V_{\mathrm{Ho}}$, divided by the distance between the midpoints of two adjacent electrodes.
(a) Use the estimated time presented above to obtain an expression for the packet transfer time in terms of the device dimensions, terminal voltages, and carrier mobility.
(b) Evaluate your answer in part a when the electrodes are $5 \mu \mathrm{~m}$ wide, the gap between electrodes is $0.1 \mu \mathrm{~m}, V_{\mathrm{Tr}}-V_{\mathrm{Ho}}$ is 2 V , and the electron mobility in the channel is $200 \mu \mathrm{~m}^{2} / \mathrm{V}$. Use reasonable values for any other parameters you need.
16.12 A certain CMOS process has a minimum gate length and width of $1.5 \mu \mathrm{~m}$ and runs off a $5-\mathrm{V}$ supply with 1-V threshold voltages. The electron mobility in the channel is $300 \mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}$; the oxide thickness is 5 nm .
(a) Assuming $K_{n}=K_{p}$ and taking $n$ to be 4 , calculate the switching time for CMOS inverters made using this process.
(b) Calculate the power delay product PDP for this same technology.
(c) Consider now scaling this process by a factor of $5 / 3$. Initially assume the supply and threshold voltages remain unchanged. Then scale them by a factor of $5 / 3$ also. Calculate the switching time and PDP for these two situations. Assume that the mobility remains the same as the oxide thickness is reduced, but be aware that in practice it may actually decrease somewhat.
16.13 In this question you will consider the effects of parasitic interconnect capacitance on the switching speeds of CMOS and $n$-MOS logic. To model the effects of this parasitic capapacitance, assume that the interconnect lines are $L_{\min }$ wide and of average length $m L_{\min }$, where $m$ is a number much greater than 1 , also assume that the thickness of the oxide under the lines is such that their capacitance per unit area is $a C_{\mathrm{ox}}^{*}$, where $a$ is a fraction much less than 1 .
(a) Derive an expression analogous to Eq. (16.45) for the switching transients in CMOS when the interconnect loading is accounted for through the model just described.
(b) Do the same as in part a for an $n$-MOS invertor.
(c) Assuming the multiplicative factors $m$ and $a$ are the same for CMOS and $n$ MOS, for what values of $m$ and $a$ does CMOS become faster than $n$-MOS. Assume $W_{n}=L_{\text {min }}$.
(d) Calculate the switching speed for CMOS and $n$-MOS inverters fabricated by the process described in Problem 16.12 when the average length of interconnect that each inverter drives is $60 \mu \mathrm{~m}$ (i.e., $m=40$ ) and when the thickness of the oxide under the interconnect lines is 600 nm (i.e., $a=0.05$ ).

## SOME <br> REPRESENTATIVE PROPERTIES OF <br> COMMON SEMICONDUCTORS

It is best to begin listings like the ones in this appendix with a word of caution. Only representative values can be given for many of the quantities listed. Some properties, like mobility, vary widely with specimen purity and quality; the numbers quoted in these cases are for typical moderately doped "good" material. Other properties, like the intrinsic carrier concentration, are hard to measure accurately and there is still disagreement in the literature; in these cases we quote the most widely accepted values.

Table A. 1 focuses on silicon, germanium, and gallium arsenide. These semiconductors are the most widely used; silicon is by far the most important commercially.

Table A.1.
Room temperature properties of silicon, germanium, and gallium arsenide

|  | Si | Ge | GaAs |
| :--- | :---: | :---: | :---: |
| $\Delta E_{g}(\mathrm{eV})$ | 1.124 | 0.67 | 1.42 |
| $n_{i}\left(\mathrm{~cm}^{-3}\right)$ | $1.08 \times 10^{10}$ | $2.4 \times 10^{13}$ | $9 \times 10^{6}$ |
| $\mu_{e}\left(\mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}\right)$ | 1500 | 3900 | 8500 |
| $\mu_{h}\left(\mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}\right)$ | 600 | 1900 | 400 |
| $\varepsilon_{r}\left(\varepsilon / \varepsilon_{0}\right)$ | 11.7 | 15.8 | 13.1 |

Table A. 2 lists some typical values for representative properties of a number of common elemental and compound semiconductors at room temperature. Looking at this table in light of the periodic table, you should notice certain trends in the properties. For example, you should see that the energy gap tends to decrease as you move down the columns of the periodic table and tends to increase as you move along the rows out from column VI. Thus the energy gap of InAs is smaller than that of InP, and that of InSb is even smaller. Similarly the energy gap of InAs is less than that of GaAs, which in turn is less than AlAs. Moving out along a row, the energy gap of GaAs is larger than that of Ge , while that of ZnSe is even larger. If you go even further out to the I-VII's (e.g., NaCl) you find that the energy gaps are so large that the materials are insulators. An opposite trend is seen in the lattice constants and to some extent in the mobilities. Other properties also show the tendency to reflect the chemistry of their constituents, and a knowledge of the periodic table can be valuable to the electronic materials engineer or scientist.

Table A. 2
Properties at room temperature ( 300 K ) of some representative elemental and compound semiconductors.

|  | Lattice |  | Energy Gap |  | Mobilities |  |
| :---: | :---: | :---: | :---: | :---: | :---: | :---: |
|  | Period $(\leftrightarrow)$ | Type | Size ( $\Delta E_{g}$ ) | Type | $\mu_{e}\left(\mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}\right)$ | $\mu_{h}\left(\mathrm{~cm}^{2} / \mathrm{V} \cdot \mathrm{s}\right)$ |
| C | 3.57 | d | 5.5 | d | 2000 | 2100 |
| Si | 5.43 | d | 1.124 | i | 1500 | 500 |
| Ge | 5.64 | d | 0.67 | i | 3900 | 1900 |
| $\mathrm{a}-\mathrm{Sn}$ | 6.49 | d | $\approx 0.08$ | d | 2500 | 2400 |
| AlP | 5.46 | z | 2.43 | i | 80 |  |
| AlAs | 5.66 | 2 | 2.17 | i | 1000 | 180 |
| AlSb | 6.13 | z | 1.58 | i | 200 | 420 |
| GaP | 5.4 | z | 2.26 | i | 300 | 150 |
| GaAs | 5.65 | $z$ | 1.42 | d | 8500 | 400 |
| GaSb | 6.09 | z | 0.72 | d | 4600 | 850 |
| InP | 5.86 | z | 1.35 | d | 4000 | 600 |
| InAs | 6.05 | z | 0.36 | d | 33,000 | 200 |
| InSb | 6.47 | z | 0.17 | d | 80,000 | 1700 |
| ZnS | 5.42 | z | 3.68 | d | 165 | 5 |
| ZnSe | 5.67 | z | 2.70 | d | 500 | 30 |
| ZnTe | 6.10 | z | 2.26 | d | 340 | 50 |
| CdS |  | w | 2.42 | d | 250 |  |
| CdSe |  | w | 1.73 | d | 650 |  |
| CdTe | 6.48 | z | 1.56 | d | 1050 | 100 |

The abbreviations used are, in the lattice type column: d-diamond, z-zinc blende, w -wurtzite (hexagonal); and in the energy gap type column: d -direct, i -indirect.

## APPENDIX B

## SEEING HOLES AND ELECTRONS

There are two basic experiments that can be performed on a semiconductor sample to determine whether it is $n$-type or $p$-type, that is, whether it contains an excess of donors or an excess of acceptors. The first experiment, called the hot point probe measurement, is a simple test that can very quickly tell us whether a sample is $n$ - or $p$-type. The second experiment, the Hall effect measurement, is more complex to implement than the hot point probe experiment, but it can tell us both the majority carrier type and concentration. By measuring the conductivity at the same time, we can also determine the majority carrier mobility. We will consider each experiment in turn.

## B. 1 HOT POINT PROBE MEASUREMENT

In the hot point probe measurement, two electrodes are used, one of which is heated to between $100^{\circ} \mathrm{C}$ and $150^{\circ} \mathrm{C}$. The heated electrode (for example, the tip of a small soldering iron) is connected to the negative input terminal of a sensitive DC ammeter. The unheated electrode is connected to the positive terminal. The two probes are then touched against the semiconductor sample to be tested, and the reading of the ammeter is monitored. This situation is illustrated in Fig. B.1. A positive current indicates a $p$-type sample, a negative current an $n$-type.

What is happening in the hot point probe experiment is that a temperature gradient is being created in the sample; the carriers tend to move down the gradient (i.e., from hot to cold). If the majority of the carriers are holes, there is a positive current within the sample that flows from the hot region to the cold electrode through the ammeter to the hot electrode. A positive current is registered on the ammeter. If the majority carriers are electrons, the flux of carriers is in the same


FIGURE B. 1
Illustration of the hot point probe experiment being performed on a $p$-type semiconductor sample.
direction, but since they are negatively charged, the current is in the opposite direction.

The motion of carriers in a temperature gradient is called the thermoelectric effect; it is also called the Thompson effect. It can be used to convert thermal energy to electrical energy and has been used in applications where other electrical power sources are impractical and/or where there is a good source of heat. Some satellites use thermoelectric power supplies heated by nuclear reactors, and small generators heated by oil burners have been developed for use in polar regions. These cells are designed to have many $p$ - and $n$-regions connected electrically in series and thermally in parallel, as pictured in Fig. B.2.

Interestingly, this device can also be operated in reverse. A current forced through a thermoelectric cell will cause one side to become hot and the other to become cold. This effect is called the Peltier effect. A device designed specifically to operate in this mode is called a Peltier, or thermoelectric, cooler.


FIGURE B. 2
Thermoelectric generator or cooler.

## B. 2 HALL EFFECT MEASUREMENT

The Hall effect measurement is performed on a bar-shaped sample with large area electrical contacts on each end and two small-area contacts in its middle on opposite sides of the sample. Two other small area contacts are usually also applied to one side of the sample; these are not part of the Hall effect measurement but are used to make a simultaneous conductivity measurement, as will be explained below. A magnetic field is applied normal to the top of the sample, as illustrated in Fig. B.3.

A current $I$ is sent through the bar from end to end, and a voltage is measured between the two small contacts opposite each other near the middle of the bar. This voltage, labeled $V_{H}$ in Fig. B.3, is the Hall voltage. It is inversely proportional to the equilibrium majority carrier concentration, as we shall see next.

Imagine that our sample is $p$-type and has an equilibrium hole concentration $p_{0}$. If a current $I$ is flowing in the bar, then the net average velocity in the $x$ direction of each of the holes is

$$
\begin{equation*}
\bar{v}_{x}=\frac{I}{q p_{o} w t} \tag{B.1}
\end{equation*}
$$

Because of the magnetic field, each of the holes will experience a force $q \boldsymbol{v} \times \boldsymbol{B}$ in the negative $y$-direction,

$$
\begin{equation*}
F_{y}^{\text {mag }}=-q v_{x} B=-\frac{I B}{p_{o} w t} \tag{B.2}
\end{equation*}
$$

and the moving holes will be deflected toward the near side of the bar in Fig. B.3.
As the charge carriers are deflected to one side of the bar they will create an electric field $\mathscr{E}_{y}$, that will eventually be strong enough to balance the force due to the magnetic field. The force due to the electric field is


FIGURE B. 3
Experimental setup of the Hall effect measurement.

$$
\begin{equation*}
F_{y}^{\mathrm{elect}}=q \mathscr{E}_{y}=\frac{q V_{H}}{w} \tag{B.3}
\end{equation*}
$$

In the steady state, these two forces will balance each other and the total force in the $y$-direction is zero.

$$
\begin{equation*}
F_{y}^{\mathrm{tot}}=\frac{q V_{H}}{w}-\frac{I B}{p_{o} w t}=0 \tag{B.4}
\end{equation*}
$$

Solving this equation for $V_{H}$, we can relate $V_{H}$ to $I, B, t$, and $p_{o}$ :

$$
\begin{equation*}
V_{H}=\frac{I B}{q p_{o} t} \tag{B.5}
\end{equation*}
$$

If the majority carriers had been electrons, they would have been moving in the negative $x$-direction:

$$
v_{x}=\frac{I}{(-q) n_{0} w t}
$$

and the force due to the magnetic field again would have deflected them to the near side of the bar:

$$
\begin{equation*}
F_{y}=-(-q) v_{x} B=-\frac{I B}{n_{0} w t} \tag{B.6}
\end{equation*}
$$

The electric field in this case is thus in the opposite direction, and the Hall voltage is negative:

$$
\begin{equation*}
V_{H}=-\frac{I B}{q n_{0} t} \tag{B.7}
\end{equation*}
$$

We see that the sign of the Hall voltage tells us the majority carrier type and, furthermore, that we can calculate the majority carrier concentration from the magnitude of the Hall voltage. If we also measure the voltage drop along the bar (i.e., $V_{R}$ in Fig. B.3), we can calculate the conductivity of the bar and then the carrier mobility. We have

$$
\begin{equation*}
V_{R}=\frac{I d}{\sigma_{o} w t} \tag{B.8}
\end{equation*}
$$

and

$$
\sigma_{o}= \begin{cases}q \mu_{h} p_{o} & \text { for } p \text {-type }  \tag{B.9a}\\ q \mu_{e} n_{o} & \text { for } n \text {-type }\end{cases}
$$

Combining these we find if the sample is $n$-type that

$$
\begin{equation*}
\mu_{e}=\frac{I d}{V_{R} w t q n_{o}} \tag{B.10}
\end{equation*}
$$

If the sample is $p$-type we find

$$
\begin{equation*}
\mu_{h}=\frac{I d}{V_{R} w t q p_{0}} \tag{B.11}
\end{equation*}
$$

We can write both Eq. (B.10) and Eq. (B.11) in terms of $V_{H}$ as

$$
\begin{array}{ll}
\mu_{e}=\frac{\left|V_{H}\right| d}{V_{R} B w} & \text { for } n \text {-type } \\
\mu_{h}=\frac{\left|V_{H}\right| d}{V_{R} B w} & \text { for } p \text {-type } \tag{B.12b}
\end{array}
$$

The Hall effect measurement is a standard materials characterization technique. Next to conductivity it is perhaps the most commonly used electrical measurement for analyzing semiconductor crystals.

# SOME IMPORTANT CONCEPTS OF SOLID-STATE PHYSICS 

In our modeling and discussions in this text, we have not needed to introduce quantum mechanical models for the energy states and transport properties of electrons in semiconductors. We have, in fact, rigorously avoided doing so, and we have been able to understand and model everything we needed to without such advanced physics. Nonetheless, the use of quantum mechanical terminology in discussing semiconductor device physics is common practice. It is consequently important that you become familiar with certain concepts of modern quantum physics if you are to go further in the study of semiconductor physics and if you are to read the technical and professional device literature. Of particular importance are the concepts of energy bands and effective mass, which are the subjects of this appendix. The discussions in this appendix can only give you the briefest introduction to these subjects. Nonetheless they will get you started and will hopefully whet your appetite and motivate you to take additional quantum and solid-state physics courses.

## C. 1 ENERGY BANDS

One of the critical steps in the progression of our present understanding of atoms and solids was the development of the atomic orbital model by Neils Bohr in 1913. This model states that electrons orbiting about an atomic nucleus can have only certain specific energies and that they occupy well-defined, discrete energy
levels. For example, in the simplest of atoms, the hydrogen atom, this model tells us that these specific energies $E_{n}$ are given by

$$
\begin{equation*}
E_{n}=-\frac{13.6}{n^{2}} \mathrm{eV} \tag{C.1}
\end{equation*}
$$

Here $n$ is an index ranging from 1 to infinity that defines the different energy levels, and the zero reference for electron energy has been taken to correspond to a situation where the electron is at rest infinitely far away from the nucleus (a proton in the case of the hydrogen atom), which is also at rest.

In this model every energy level represents a possible location, or state, for two electrons, one we identify as having spin $+\frac{1}{2}$, and the other spin $-\frac{1}{2}$. Spin is another index, like $n$, that describes a characteristic (in this case, a rotational characteristic) of electrons.

For atoms more complicated than the hydrogen atom, the distribution of energy levels and their calculation is more complex, but the basic model of welldefined, discrete energy levels is maintained. These discrete energy levels are identified by a series of indices, such as $n$ and spin, that are called quantum numbers.

When atoms are combined to form molecules, the components of the individual atoms (i.e., electrons, protons, and neutrons) interact and the energy levels of the individual atoms are modified; they evolve into the energy levels of the molecule. The total number of possible states is unchanged, but their energies are shifted from their original values. For example, when a hydrogen molecule is formed from two hydrogen atoms, the $n=1$ levels of the two isolated hydrogen atoms become two closely spaced levels near -13.6 eV in the hydrogen molecule. This evolution is illustrated in Fig. C.1. Although not shown in this figure, the other energy levels split similarly. Note, however, that the energy levels with higher $n$ values, which correspond to electrons in orbitals with larger radii, split more because the electrons in these larger "outer" orbitals interact more with the


FIGURE C. 1
Schematic comparison of the energy levels of a hydrogen atom and a hydrogen molecule, illustrating the modification of the atomic energy levels by the formation of a molecule.


FIGURE C. 2
Representation of the evolution of the discrete atomic energy levels of isolated atoms into the tightly spaced bands of energy levels in a solid.
electrons of the neighboring atom than do the electrons in the smaller "inner" orbitals.

When many atoms come together to form a solid, the energy levels of the individual atoms coalesce into bands of closely spaced energy levels, as is illustrated in Fig. C.2. The electrons in low-lying energy levels, corresponding to orbitals nearer to the atomic nuclei, do not interact much, and these levels form a relatively narrow band. The higher-energy electrons-those in larger radii ("outer" orbitals)-interact more, resulting in the spreading of their energy levels into a wider band. Some of the higher bands spread so much that they overlap other bands, and some of the overlapping bands mix so much that the identities of the original atomic levels from which they evolved is completely obscured.

In summary, the picture of energy levels in a solid looks quite different from that of an atom and consists of a series of energy bands, each band containing many closely spread energy levels that electrons can occupy, two to a level, one with spin "up" and one with spin "down."

A common way of presenting information on the distribution of electron energy levels in a solid is to plot the density of levels as a function of energy. We plot what is termed the density of states $\rho(E)$ versus the electron energy $E$, as illustrated in Fig. C.3. The units of $\rho(E)$ are number of states per $\mathrm{eV} \cdot \mathrm{cm}^{3}$.

Knowing the density of states function $\rho(E)$ gives us a model for where electrons can be, but it doesn't tell us where they actually are. To determine where the electrons are, we have to model how the electrons in the solid are distributed among the possible states. For this it is necessary to turn to statistical mechanics and to develop a model for the probability of finding an electron in a particular energy level. When this is done we find that the probability distribution appropriate to electrons is something called the Fermi distribution function $f(E)$, given by


Density of states $\rho(E)$

FIGURE C. 3
Representative plot of the density of states for electrons as a function of the electron energy in a typical crystalline solid such as silicon.

$$
\begin{equation*}
f(E)=\frac{1}{\left[1+e^{\left(E-E_{f}\right) / k T}\right]} \tag{C.2}
\end{equation*}
$$

where the parameter $E_{f}$ is called the Fermi energy. We will discuss how $E_{f}$ is determined shortly, but it is first instructive to look at some of the general properties of the Fermi distribution function. This function is plotted for several values of $k T$ in Fig. C.4. We note that the function $f(E)$ is nearly 1 for $E \ll E_{f}$ and is nearly 0 for $E \gg E_{f}$; it is exactly $\frac{1}{2}$ for $E$ exactly equal to $E_{f}$.


FIGURE C. 4
Plot of the Fermi distribution function versus the electron energy for several temperatures to illustrate the general shape of this function as well as its evolution as the temperature is increased.

More quantitatively, when $E$ is several $k T$ less than $E_{f}, f(E)$ can be approximated as

$$
\begin{equation*}
f(E) \approx 1-e^{\left(E-E_{f}\right) / k T} \quad \text { for }\left(E-E_{f}\right) \ll-k T \tag{C.3a}
\end{equation*}
$$

and when $E$ is several $k T$ greater than $E_{f}, f(E)$ is approximately

$$
\begin{equation*}
f(E) \approx e^{\left(E-E_{f}\right) / k T} \quad \text { for }\left(E-E_{f}\right) \gg k T \tag{C.4}
\end{equation*}
$$

These expressions should have a familiar look, especially if we write the first in terms of the probability of not finding an electron in a state well below $E_{f}$. This is simply $1-f(E)$, which is

$$
\begin{equation*}
1-f(E) \approx e^{-\left(E-E_{f} / k T\right)} \quad \text { for }\left(E-E_{f}\right) \ll-k T \tag{C.3b}
\end{equation*}
$$

Written this way, Eqs. (C.3b) and (C.4) bear a striking similarity to Eq. (6.7) and (6.8), and we shall have more to say about this shortly.

Note, finally, the very high symmetry of $f(E)$ about the point $\left(E_{f}, 0.5\right)$. It is easy to show that

$$
\begin{equation*}
f\left(E_{f}+E_{0}\right)=1-f\left(E_{f}-E_{0}\right) \tag{C.5}
\end{equation*}
$$

which says simply that the probability of finding an electron at an energy $E_{0}$ above $E_{f}$ equals the probability of not finding it at an energy $E_{0}$ below $E_{f}$.

The density of electrons with energies between $E$ and $E+d E$ in a material with a density of states function $\rho(E)$ is given by the product of $\rho(E)$ and the probability function $f(E)$, that is,

$$
\begin{equation*}
n(E) d E=f(E) \rho(E) d E \tag{C.6}
\end{equation*}
$$

The term $n(E)$ has units of number of electrons per $\mathrm{eV} \cdot \mathrm{cm}^{3}$.
Up to this point in our discussion the Fermi energy $E_{f}$ is still unspecified, but we are now in a position to determine what it is. We determine $E_{f}$ by insisting that the sum of $n(E) d E$ over all $E$ is $n_{\text {TOT }}$, the total number of electrons per unit volume (i.e., the density of atoms times the number of electrons per atom), in the semiconductor we are modeling:

$$
\begin{equation*}
n_{\mathrm{TOT}}=\int_{-\infty}^{\infty} f(E) \rho(E) d E \tag{C.7}
\end{equation*}
$$

Since the only unknown that enters into Eq. (C.7) is $E_{f}$, the above equation effectively specifies the value of $E_{f}$.

Physically we can think of the Fermi energy $E_{f}$ as the energy value to which the available electron energy levels in a solid are, on average, filled. Referring to Fig. C.4, we see that there is little probability of finding an electron in a state much above $E_{f}$, whereas there is a virtual certainty of finding electrons in all of the states well below $E_{f}$. The probabilities we refer to here are, of course, all dependent on temperature because all energy differences are referenced to $k T$ in our expressions and because the lower the temperature, the more abrupt is the step in $f(E)$ (see Fig. C.4). In the extreme of absolute zero temperature, $0 \mathrm{~K}, f(E)$ is identically 1 for $E$ below $E_{f}$ and 0 above $E_{f}$, so all of the states below $E_{f}$ are
filled and all of the states above $E_{f}$ are empty. At higher temperatures, electrons from some of the levels below $E_{f}$ acquire enough energy from the lattice to occupy energy lèvels above $E_{f}$.

In a semiconductor the Fermi level typically falls between two bands of energy levels. The lower band, called the valence band, corresponds to the energies of electrons in the bonding orbitals, or states, of the crystal (i.e., in the covalent bonds in silicon). The upper band, the conduction band, corresponds to the energies of electrons that can move throughout the crystal lattice. The upper edge of the valence band is called the valence band energy $E_{v}$; the lower edge of the conduction band is called the conduction band energy $E_{c}$. The difference between these two energies is called the energy gap $\Delta E_{g}$. These quantities are illustrated in Fig. C.5, which diagrams the density of states function of a representative semiconductor in the vicinity of the energy gap. Also indicated on this figure are representative donor and acceptor energies. Notice that $\rho(E)$ decreases to zero at the band edges and increases going away from the edge and "into" the band. This variation is often approximated as being parabolic for purposes of performing calculations with $\rho(E)$.

We are now actually in a position to calculate the Fermi energy and carrier concentration using our new models and to compare the results with our discussion in Chap. 2. Before doing this, however, it is a useful first exercise to reason through what the Fermi energy is qualitatively in several representative situations.


FIGURE C. 5
Density of states for a typical semiconductor in the vicinity of the energy gap. The conduction band edge energy $E_{c}$ and valence band energy $E_{v}$ are both illustrated, as are the positions of typical donor and acceptor energies, $E_{d}$ and $E_{a}$, respectively.

In doing so it is often helpful to first find $E_{f}$ near 0 K and then to see what it is at higher temperatures. Consider first an intrinsic semiconductor. In an intrinsic semiconductor at 0 K , all of the valence band states are occupied and all of the conduction band states are empty. Thus $E_{f}$ clearly falls somewhere between $E_{v}$ and $E_{c}$. We can reason that it must be near the middle of the energy gap [i.e., near $\left.\left(E_{v}+E_{c}\right) / 2\right]$ because of the symmetry of $f(E)$ evident in Fig. C. 4 and pointed out in Eq. (C.5). Above 0 K the intrinsic population of electrons in the conduction band equals the population of empty states in the valence band, which means that the probability of finding electrons above $E_{c}$ must be the same as the probability of not finding them below $E_{v}$. Thus we must have $E_{f}$ roughly halfway between $E_{\nu}$ and $E_{c}$ at all temperatures in an intrinsic sample. We call this energy $E i$, and this behavior is illustrated in Fig. C. 6 by the curve labeled A. Note that the horizontal axis in this plot is $1 / T$.

Next consider a sample with $N_{d}$ donor states with energies clustered about $E_{d}$. At 0 K all of the donor states are occupied and there are no conduction electrons, so $E_{f}$ must fall somewhere between $E_{d}$ and $E_{c}$, as the curve labeled $B$ in Fig. C. 6 illustrates. At higher temperatures, $E_{f}$ must decrease until at room temperature it is several $k T$ below $E_{d}$. Nonetheless, it remains much nearer to the donor level $E_{d}$ than to the valence band edge $E_{\nu}$. If you think a bit more about this picture you may be terribly bothered by the fact that the donor states are expected to be largely unoccupied (i.e., ionized) while the higher conduction band states are occupied by $N_{d}$ electrons, even though the probability of these conduction band states being occupied is lower than it is for the donor states. The solution to this puzzle lies in the numbers: there are far, far more conduction band states than donor states (in samples for which this approximation-full ionization of donor states at room temperature-is valid), so the product of the density of


FIGURE C. 6
Values of the Fermi energy $E_{f}$ as a function of inverse temperature $1 / T$ in four different situations. Curve A represents intrinsic material, $N_{d}=N_{a}=0$; Curve B represents $n$-type material, $N_{d} \neq 0, N_{a}=0$; Curve C represents $p$-type material, $N_{d}=0, N_{a} \neq 0$; and Curve D represents compensated material that is net $n$-type, $N_{d} \neq 0, N_{a} \neq 0, N_{d}-N_{a}>0$.
states times the probability is still $N_{d}$ even though the probability of any one state being occupied is very small. At very large temperatures, well above room temperature, the Fermi level moves down well into the energy gap and the sample again looks intrinsic (recall Fig. 2.9; the curve in this figure was calculated using precisely the models we are describing in this appendix). This is also illustrated by the curve labeled $B$ in Fig. C.6.

Similar arguments can be used to determine $E_{f}$ in a sample containing $N_{a}$ acceptors and also in samples containing both donors and acceptors. You may want to try it yourself and to compare your results with the curves labeled $C$ and $D$ in Fig. C. 6.

Next we turn to the issue of relating the discussion in this appendix to the models we developed in Chap. 6 in which we related the thermal equilibrium carrier populations to the electrostatic potential $\phi$ [i.e., Eqs. (6.7) and (6.8), which we repeat here]:

$$
\begin{align*}
& n_{0}=n_{i} e^{q \phi / k T}  \tag{6.7}\\
& p_{0}=n_{i} e^{-q \phi / k T} \tag{6.8}
\end{align*}
$$

Using our present model we can calculate the total number of conduction electrons, $n_{o}$, by integrating $n(E) d E$ over all $E$ greater than $E_{c}$. Using Eq. (C.7) we have

$$
\begin{equation*}
n_{o}=\int_{E_{c}}^{\infty} f(E) \rho(E) d E \tag{C.8}
\end{equation*}
$$

Assuming that $E_{c}-E_{f}$ is greater than several $k T$, we can use Eq. (C.4) for $f(E)$ and write

$$
\begin{equation*}
n_{o} \approx \int_{E_{c}}^{\infty} \rho(E) e^{-\left(E-E_{f}\right) / k T} d E \tag{C.9}
\end{equation*}
$$

which we can rewrite as

$$
\begin{equation*}
n_{o}=e^{-\left(E_{c}-E_{f}\right) / k T} \int_{E_{c}}^{\infty} \rho(E) e^{-\left(E-E_{c}\right) / k T} d E \tag{C.10}
\end{equation*}
$$

This is an attractive format because the integral is now independent of $E_{f}$ and thus is an intrinsic property of the semiconductor. We define this integral as the effective density of states in the conduction band, $N_{c}(T)$ :

$$
\begin{equation*}
N_{c}(T) \equiv \int_{E_{c}}^{\infty} \rho(E) e^{-\left(E-E_{c}\right) / k T} d E \tag{C.11}
\end{equation*}
$$

We thus write

$$
\begin{equation*}
n_{0}=N_{c}(T) e^{-\left(E_{c}-E_{f}\right) / k T} \tag{C.12}
\end{equation*}
$$

Using similar reasoning we can define an effective density of states in the valence band, $N_{\nu}(T)$. This time, however, we are concerned with the number of states below $E_{v}$, that are unoccupied. Thus we have

$$
\begin{equation*}
p_{0}=\int_{-\infty}^{E_{y}} \rho(E)[1-f(E)] d E \tag{C.13}
\end{equation*}
$$

Assuming that $E_{f}-E_{v}$ is positive and greater than several $k T$, we use Eq.(C.3) to arrive at

$$
\begin{equation*}
p_{o}=N_{v}(T) e^{-\left(E_{f}-E_{v}\right) / k T} \tag{C.14}
\end{equation*}
$$

where the effective density of states in the valence band, $N_{\nu}(T)$, is given by

$$
\begin{equation*}
N_{v}(T)=\int_{-\infty}^{E_{v}} \rho(E) e^{-\left(E_{v}-E\right) / k T} d E \tag{C.15}
\end{equation*}
$$

In Eq. (6.7) and (6.8), $n_{0}$ and $p_{0}$ are expressed in terms of the intrinsic carrier concentration $n_{i}$ rather than $E_{f}$, so it is logical to next turn to finding an expression for $n_{i}$. In an intrinsic sample, $n_{i}=n_{o}=p_{o}$; thus if we call $E_{f}$ in intrinsic material $E_{i}$, we have

$$
\begin{equation*}
n_{i}=N_{c}(T) e^{-\left(E_{c}-E_{i}\right) / k T}=N_{\nu}(T) e^{-\left(E_{i}-E_{v}\right) / k T} \tag{C.16}
\end{equation*}
$$

Solving this equation for $E_{i}$, we have

$$
\begin{equation*}
e^{E_{i} / k T}=\sqrt{\frac{N_{v}(T)}{N_{c}(T)}} e^{\left(E_{c}+E_{v}\right) / 2 k T} \tag{C.17a}
\end{equation*}
$$

or

$$
\begin{equation*}
E_{i}=\frac{\left(E_{\mathrm{c}}+E_{\nu}\right)}{2}+\frac{\left[\ln \left(N_{v} / N_{\mathcal{C}}\right)\right]}{2} \tag{C.17b}
\end{equation*}
$$

Using the first expression in Eq. (C.17), we find

$$
\begin{equation*}
n_{i}(T)=\sqrt{N_{c}(T) N_{v}(T)} e^{-\left(E_{c}-E_{v}\right) / 2 k T} \tag{C.18}
\end{equation*}
$$

Notice that $n_{i}(T)$ depends only on intrinsic material parameters and temperature; it does not depend on the doping levels, just as we argued must be the case in Chap. 2.

Notice also from Eqs. (C.12) and (C.14) that the $n_{o} p_{o}$ product is $n_{1}^{2}$. This is reassuring, but you should realize that the relative simplicity of these two equations and this result depend on $E_{f}$ being well within the energy gap, far away from either band edge (i.e., $E_{v} \ll E_{f} \ll E_{c}$, where " $<$ " indicates several $k T$ ). If the semiconductor under question is so heavily doped, either $n$-type or $p$-type, that this is no longer the case, then the $n_{o} p_{0}$ product will no longer be simply $n_{1}^{2}$. Recalling our discussions in Chap. 2, we had in fact indicated that this would be the case, but we were unable to quantify that argument. Now we are in a position to do so. Clearly when the net donor (or acceptor) concentration
gets to within a factor of 10 of the effective density of states in the conduction (or valence) band, we should anticipate problems with the simple model.

Finally, you should compare Eq. (C.18) with Eq. (2.29a), keeping in mind that $E_{c}-E_{v}$ is $\Delta E_{g}$. If we had developed a sufficiently detailed model for $\rho(E)$ we would have also found that $N_{c}(T)$ and $N_{v}(T)$ each vary as $T^{3 / 2}$.

We next rewrite Eqs. (C.12) and (C.14) using Eq. (C.18) for $n_{i}$. Doing this yields

$$
\begin{align*}
& n_{o}=n_{i} e^{\left[E_{f}-\left(E_{c}+E_{v}\right) / 2+\left(\ln N_{c} / N_{v}\right) / 2\right] / k T}  \tag{C.19a}\\
& p_{o}=n_{i} e^{-\left[E_{f}-\left(E_{c}+E_{v}\right) / 2+\left(\ln N_{c} / N_{v}\right) / 2\right] / k T} \tag{C.19b}
\end{align*}
$$

We have already identified the quantity $\left(E_{c}+E_{v}\right) / 2+\left(\ln N_{c} / N_{v}\right) / 2$ as the Fermi level in intrinsic material, $E_{i}$, so we in fact have

$$
\begin{align*}
& n_{0}=n_{i} e^{\left(E_{f}-E_{i}\right) / k T}  \tag{C.20a}\\
& p_{o}=n_{i} e^{-\left(E_{f}-E_{i}\right) / k T} \tag{C.20b}
\end{align*}
$$

Comparing these expressions to Eqs. (6.7) and (6.8), we see that the electrostatic potential in a semiconductor, $\phi$, is equivalent to the difference between the Fermi level and its value in intrinsic material (with a suitable factor of $q$ included to convert from potential to energy), that is,

$$
\begin{equation*}
\phi=\frac{\left(E_{f}-E_{i}\right)}{q} \tag{C.21}
\end{equation*}
$$

Thus far we have obtained expressions for the equilibrium carrier concentrations in a uniformly doped semiconductor given the Fermi energy [Eqs. (C.12) and (C.14) or Eqs. (C.20a) and (C.20b)], but except for the case of intrinsic material, we do not yet know how to find the Fermi energy given the dopant concentrations. We are, however, now in a position to do just that. In fact, we can calculate the thermal equilibrium Fermi energy and carrier concentrations in a uniformly doped semiconductor if we know the doping concentration and dopant energies, even at low temperatures where all of the dopants are not ionized and at very high temperatures where there is an appreciable intrinsic concentration.

The starting point for such a calculation is Eq. (2.8), which we rewrite here as

$$
\begin{equation*}
p_{o}+N_{d}^{+}-n_{o}-N_{a}^{-}=0 \tag{C.22}
\end{equation*}
$$

Eqs. (C.20a) and (C.20b) provide us with expressions for $p_{o}$ and $n_{o}$ in terms of the unknown $E_{f}$. We simply need to write $N_{d}^{+}$and $N_{a}^{-}$in terms of $E_{f}$ and we will have one equation we can solve for $E_{f}$.

The Fermi function for dopant atoms is slightly different than the Fermi function for bulk levels, and the number of occupied donor states, or $\left(N_{d}-N_{d}^{+}\right)$, is given by

$$
\begin{equation*}
N_{d}-N_{d}^{+}=\frac{N_{d}}{\left[1+g_{d} e^{\left(E_{d}-E_{f}\right) / k T}\right]} \tag{C.23a}
\end{equation*}
$$

where the new factor $g_{d}$ takes on values ranging from 0.5 to 2 depending on the nature of the donor. (This factor is often ignored since doing so contributes an error on the order of only $k T$ to the final result.) Similarly, the number of occupied (ionized) acceptors is

$$
\begin{equation*}
\bar{N}_{a}=\frac{N_{a}}{\left[1+g_{a} e^{\left(E_{d}-E_{f}\right) / k T}\right]} \tag{C.23b}
\end{equation*}
$$

where the factor $g_{a}$ is on the order of 1 and is also often ignored.
Combining these two equations in Eq. (C.22) with our equations for $n_{0}$ and $p_{0}$ gives us the expression we need to solve to find $E_{f}$ :

$$
\begin{gather*}
n_{i} e^{\left(E_{f}-E_{i}\right) / k T}+N_{d}\left\{1-\frac{1}{\left[1+g_{d} e^{\left(E_{d}-E_{f}\right) / k T}\right]}\right\} \\
-n_{i} e^{\left(E_{f}-E_{i}\right) / k T}-\frac{N_{a}}{\left[1+g_{a} e^{\left(E_{a}-E_{f}\right) / k T}\right]}=0 \tag{C.24}
\end{gather*}
$$

In any given situation this expression can be simplified greatly by approximating the Fermi function terms as we did in Eqs. (C.3) and (C.4). Often, an analytical expression can even be obtained. In any event, we can solve for $E_{f}$ either numerically or analytically, and if we have $E_{f}$ we can also calculate $n_{0}, p_{0}, N_{d}^{+}$, and $N_{a}^{-}$.

Thus far we have restricted our discussion in this appendix to thermal equilibrium and uniformly doped semiconductors. Strictly speaking, the Fermi distribution applies only in thermal equilibrium, which explains our insistence on equilibrium, but there is no reason we cannot treat nonuniformly doped samples in thermal equilibrium. In doing this, the most important thing to realize is that even though the doping varies spatially and therefore there are built-in fields and variations in the electrostatic potential, the Fermi energy must be constant and independent of position. That is,

$$
\frac{\partial E_{f}}{\partial x}=0
$$

To understand that this must be the case, recall the origin of $E_{f}$ : the Fermi distribution function tells us the probability of finding an electron with a given energy. In thermal equilibrium the probability of finding an electron at energy $E_{1}$ at site $x_{A}$ must be the same as that of finding an electron at the same energy $E_{1}$ at $x_{B}$. If not, the carriers at $x_{B}$ would tend to move to $x_{A}$, or vice versa, a situation that is inconsistent with thermal equilibrium. Thus, $E_{f}$ must be independent of position in thermal equilibrium.

To proceed, we rewrite Eq. (C.21) in thermal equilibrium using this fact:

$$
q \phi(x)=E_{f}-E_{i}(x) \text { in the thermal equilibrium }
$$



FIGURE C. 7
(a) Plot of the electrostatic potential through a $p-n$ junction in thermal equilibrium; (b) the corresponding plot of the energy band profile through the same junction.

We next recall that we already know how to determine $\phi(x)$ in nonuniform situations, such as in a $p-n$ junction, and thus we know $E_{i}(x)$. It is useful to rewrite Eq. (C.21) in this light.

$$
E_{i}(x)=E_{f}+(-q) \phi(x)
$$

In rewriting Eq. (C.21') we have also tried to bring out the idea that at any position $x$, the energy level picture of the semiconductor under consideration is shifted up and/or down, relative to a reference level, by the electrostatic potential energy of the electrons at that point, $(-q) \phi(x)$. To emphasize this result, we present both the electrostatic potential profile and the energy level profile through a $p-n$ junction in Fig. C.7. The electrostatic potential picture, Fig. C.7a, is just repeated from Fig. 6.5c. In the corresponding energy level plot, Fig. C.7b, we have plotted not only $E_{i}(x)$ but the band-edge energies $E_{c}(x)$ and $E_{v}(x)$ as well. These energies track $E_{i}(x)$ exactly, so they do not provide new information in


FIGURE C. 8
Energy level profile in two semiconductor device structures under mild applied biases: (a) a uniformly doped bar; (b) a p-n junction.
that sense, but since the hole and electron populations depend on the proximity of the band edges to the Fermi energy, you can more easily get an idea of how the carrier populations vary spatially when $E_{c}$ and $E_{v}$ are included in the figure. Plots like those in Fig. C. $7 b$ are widely used by device engineers.

We said earlier that the Fermi function is, strictly speaking, valid only in thermal equilibrium. Nonetheless it can be extended to quasiequilibrium situations if we are careful. Doing so is well beyond our mission in this text, however, and we want to consider only small excursions away from equilibrium here before stopping. When we externally impose a potential difference between two positions, $x_{\mathrm{A}}$ and $x_{\mathrm{B}}$, in a sample, what we are doing is creating a difference of $-q v_{\mathrm{AB}}$ in the Fermi energies at those two positions; that is,

$$
\begin{equation*}
E_{f}\left(x_{\mathrm{A}}\right)-E_{f}\left(x_{\mathrm{B}}\right)=q v_{\mathrm{AB}} \tag{C.25}
\end{equation*}
$$

With this observation you can now begin to extend band profile pictures like that in Fig. C. 7 to situations with an applied bias. Two examples, a uniformly doped bar of semiconductor (i.e., a resistor) and a forward-biased $p-n$ junction, are shown in Figs. C. $8 a$ and $b$, respectively.

## C. 2 EFFECTIVE MASS THEORY

The problem of describing the motion of an electron through a semiconductor seems at first to be an enormous task given the high density of atoms in a solid and the apparently numerous opportunities for collisions and deflections. The highly ordered, periodic nature of the crystal lattice simplifies the problem tremendously, however. In particular, we find that if the crystal is perfect and infinite with all of the atoms fixed in their proper positions, then the conduction electrons can be modeled as particles that move through the lattice without suffering any collisions or deflections. They move essentially as though they were traveling in free space. The only difference is that rather than accelerating in response to external forces as though they had the free space electron mass, the electrons respond as if they had a different mass. This mass, which we call the electron effective mass $m_{e}^{*}$, is usually less than the free electron mass, and contains all of the effects of the perfect crystal lattice on the carrier motion.

The model that yields this result is called the effective mass model, and it is the theoretical basis for all of our intuitive pictures of electrons and holes in semiconductors. In the case of electrons, the effective mass model tells us, as we have just said, that we can model conduction electrons in a semiconductor as particles in free space with a mass $m_{e}^{*}$ and a net charge $-q$. We call these new particles electrons also, but we must be careful to remember that they are not really electrons but rather are some sort of quasiparticle that looks and behaves much like an electron.

In the effective mass picture, defects in the perfect lattice structure introduce objects in the path of the electrons with which they can collide. For example, an impurity atom occupying the site in a silicon crystal that would normally be occupied by a silicon atom would be modeled as a sphere fixed in free space. An electron traveling through the crystal can collide with or be deflected by this object. This idea is illustrated in Fig. C.9.

The concept of a hole is another very important result of the effective mass model. According to this model, an unoccupied state in the valence band (i.e., an unoccupied covalent bond in the lattice) can also be modeled as a particle traveling in free space. This particle has a positive mass, now called the hole effective mass $m_{h}^{*}$, and it has a positive charge $+q$. As was the case with electrons, holes, too, can collide with and be deflected by defects in the crystal.

The vibrations of the lattice atoms about their equilibrium positions, which are always happening at finite temperature, are also "defects" in the perfectly periodic lattice, and they can also deflect or scatter electrons and holes moving through a crystal. These lattice vibrations can themselves be modeled as objects, called phonons, with which the charge carriers interact (i.e., collide and scatter). The number of phonons increases as the temperature increases, so the holes and electrons suffer more collisions with phonons at higher temperatures. This leads to a decrease in the mobility of the carriers at higher temperatures, as we discussed in Sec. 3.1.3.

In summary, the effective mass model is one of the most amazing results of solid-state physics, but we seldom even think about it in most of our dealings with


FIGURE C. 9
Two possible pictures of an electron moving through a crystal lattice: (a) the classical picture of a conventional electron in a periodic grid of obstacles (the lattice atoms) containing an occasional additional obstacle (defects); (b) the effective mass picture of an electron with a different mass, $m_{e}^{*}$, moving in free space and encountering occasional obstacles.
semiconductors and devices. That conduction electrons and mobile holes exist in a semiconductor is just taken for granted, and yet holes and electrons are also models. It is perhaps a testimonial to the importance of the effective mass model that we rarely even question the appropriateness of using it in our dealings with semiconductors and device structures. It is unlikely that you can fully appreciate this at this stage in your career, but the more you learn about solid-state physics and semiconductor devices, the more you will be impressed by the ubiquitousness of this model and the amazing breadth of structures and situations in which it is useful.

## APPENDIX

 D
## QUANTIFYING THE TENDENCY TO QUASINEUTRALITY

One way to begin to develop an intuitive feel for the strength of quasineutrality and to associate temporal and spatial dimensions with this phenomenon is to look at the excess majority carrier population. The population of majority carriers is very large compared to that of the minority carriers (assuming low-level injection), and this population can readily adjust itself as necessary to try to neutralize any charge imbalances. As we discussed in Chap.5, any deviation from charge neutrality will create an electric field, which will in turn cause a drift flux of majority charge carriers in such a direction as to restore neutrality.

To quantify this argument, we focus on the excess majority carrier holes in a uniformly doped $p$-type semiconductor under low-level excitation. We begin by rewriting Eqs. (5.16), (5.18), and (5.19) here as

$$
\begin{align*}
J_{h} & =\sigma_{o} \mathscr{E}-q D_{h} \frac{\partial p^{\prime}}{\partial x}  \tag{D.1}\\
\frac{\partial p^{\prime}}{\partial t} & =g_{l}-\frac{n^{\prime}}{\tau_{e}}-\frac{1}{q} \frac{\partial J_{h}}{\partial x}  \tag{D.2}\\
\varepsilon \frac{\partial \mathscr{E}}{\partial x} & =q\left(p^{\prime}-n^{\prime}\right) \tag{D.3}
\end{align*}
$$

Combining these we obtain

$$
\begin{equation*}
\frac{\partial p^{\prime}}{\partial t}=g_{l}-\frac{n^{\prime}}{\tau_{e}}-\frac{\sigma_{o}}{\varepsilon}\left(p^{\prime}-n^{\prime}\right)+D_{h} \frac{\partial^{2} p^{\prime}}{\partial x^{2}} \tag{D.4}
\end{equation*}
$$

We define the dielectric relaxation time $\tau_{D}$ as

$$
\begin{equation*}
\tau_{D} \equiv \frac{\varepsilon}{\sigma_{o}} \tag{D.5}
\end{equation*}
$$

We can rearrange Eq. (D.4), collecting the terms involving $p^{\prime}$ on one side, to obtain

$$
\begin{equation*}
\frac{\partial p^{\prime}}{\partial t}-D_{h} \frac{\partial^{2} p^{\prime}}{\partial x^{2}}+\frac{p^{\prime}}{\tau_{D}}=g_{l}+n^{\prime}\left(\frac{1}{\tau_{D}}-\frac{1}{\tau_{e}}\right) \tag{D.6}
\end{equation*}
$$

This way of writing this equation suggests that we can view the excess minority carrier population, along with any external generation process $g_{l}$, as a driving function for the majority carrier population. This is another way of stating that the majority carrier population adjusts itself to counteract deviations from neutrality. Equation (D.6) says that $p^{\prime}$ tracks $n^{\prime}$ and gives us the information we need to quantify how well it tracks. To do this we look at the homogeneous solutions to Equation (D.6) in two special cases, uniform time-varying excitation and nonuniform static excitation.

## D. 1 UNIFORM TIME-VARYING EXCITATION: $\tau_{D}$

If there is no spatial variation of $g_{l}$ or $n^{\prime}$, then the gradient term must be zero and the homogeneous equation is

$$
\begin{equation*}
\frac{d p^{\prime}}{d t}+\frac{p^{\prime}}{\tau_{D}}=O \tag{D.7}
\end{equation*}
$$

The homogeneous solution is therefore

$$
\begin{equation*}
p^{\prime}(t)=A e^{-t / \tau_{D}} \tag{D.8}
\end{equation*}
$$

which tells us that $p^{\prime}$ tracks driving functions temporally on a time scale comparable to $\tau_{D}$. If $n^{\prime}(t)$ varies with time more slowly than this, $p^{\prime}(t)$ will follow it closely and quasineutrality will hold (i.e. will be a good assumption). This is illustrated in Fig.D.1a, where the response of $p^{\prime}$ to a temporal step change in $n^{\prime}$ is shown.

(a)

(b)

FIGURE D. 1
Variations of the excess majority carrier concentration $p^{\prime}(x)$ (solid curve) in response to a hypothetical temporal or spatial step change, respectively, in the minority carrier concentration $\mathrm{n}^{\prime}(x)$ (dashed curve): (a) temporal; (b) spatial.

## D. 2 NON-UNIFORM STATIC EXCITATION: $L_{D e}$

If there is no variation of $g_{l}$ and $n^{\prime}$ with time, then the homogeneous equation of interest is

$$
\begin{equation*}
\frac{d^{2} p^{\prime}}{d x^{2}}-\frac{p^{\prime}}{D_{e} \tau_{D}}=0 \tag{D.9}
\end{equation*}
$$

The homogeneous solution is

$$
\begin{equation*}
p^{\prime}(x)=B e^{x / L_{\mathrm{De}}}+C e^{-x / L_{\mathrm{De}}} \tag{D.10}
\end{equation*}
$$

where we have defined the extrinsic Debye length $L_{\mathrm{De}}$ as $\sqrt{D_{e} \tau_{D}}$. This result teaches us that $p^{\prime}$ will track its driving functions spatially on a distance scale comparable to $L_{\mathrm{De}}$. If $n^{\prime}(x)$ varies appreciably only over distances larger than this, $p^{\prime}(x)$ will follow it closely and again the assumption of quasineutrality with hold. Figure D. $1 b$ illustrates this concept.

To summarize the discussion of this appendix, we have found that two characteristic parameters, the extrinisic Debye length $L_{D e}$ and the dielectric relaxation time $\tau_{D}$ provide us with reference meters by which we can judge whether quasineutrality is likely to be a good assumption in uniformly doped samples in which the excitations and/or excess carrier populations vary either spatially or temporally. This result can be looked at in several ways. On the one hand, we can say that if not much happens on a time period of $\tau_{D}$ or if things vary little over a distance $L_{\mathrm{De}}$, then quasineutrality is probably a good assumption. Alternatively, we can say that if things do change more rapidly than this, then we should expect quasineutrality to be restored within a few $\tau_{D}$ after a rapid temporal change and within several $L_{\mathrm{De}}$ on either side of a rapid spatial change.

Metals are generally put on semiconductors with the intent to form either lowresistance ohmic contacts or high-quality, highly rectifying diodes. However, when an arbitrary combination of metal and semiconductor is placed in contact the result is more typically an electrical union with a current-voltage characteristic that is rather nonlinear but not highly rectifying and certainly not ohmic. Thus, like most things in life, the interface between a metal and a semiconductor is not simple, and careful engineering is required to ensure that the desired result is obtained when a metal-semiconductor junction is formed. In this appendix we will take a beginning look at the metal-semiconductor junction, its variety of electrical properties, and the engineering of its characteristics to obtain either strong rectification or lowresistance linearity.

## E. 1 THE METAL-SEMICONDUCTOR JUNCTION IN THERMAL EQUILIBRIUM

In Chap. 6, when we first discussed putting electrical contacts on semiconductors (see Sec. 6.4), we stated that there is in general a difference in electrostatic potential between a metal and a semiconductor. This potential difference is usually such that a depletion region is formed in the semiconductor adjacent to the metal. Simultaneously, a thin layer of charge is induced on the adjacent surface of the metal; this charge is positive if the metal is on a $p$-type semiconductor
(in which the depletion region is negatively charged) and negative if it is on an $n$-type semiconductor (with positive depletion region charge).

We argue that the layer of charge in the metal is extremely thin because there is a very large density of mobile carriers and fixed ions in a metal (i.e., one of each per atom, or roughly $10^{22} \mathrm{~cm}^{-3}$ ). Thus a small readjustment of the carriers over only a few tens of angstroms in the metal can easily yield the net charge needed to balance the semiconductor charge. The charged layer in the metal is always much thinner than the depletion region in the semiconductor, and we usually model it as a sheet of charge on the surface of the metal, that is, as a spatial impulse of charge in the direction normal to the surface at the metal-semiconductor interface.

We model the charge in the semiconductor near a metal-semiconductor interface using the depletion approximation; that is, by assuming that the mobile carriers are fully depleted from a region $x_{d}$ wide and that deeper into the material quasineutrality holds. The resulting net charge distribution is illustrated in Fig. $\mathrm{E} .1 a$ and $b$ for metals on $n$ - and $p$-type semiconductors, respectively.

Proceeding as we did in the depletion approximation model for a $p-n$ junction in thermal equilibrium, we integrate the net charge density once to get the electrical field distribution. For a structure made on an $n$-type semiconductor, the net charge density is $+q N_{d}$ between 0 and $x_{d}$, there is an impulse of charge with intensity $-q N_{d} x_{d}$ at the metal surface, and there is zero net charge elsewhere. Thus we find that the electric field is

$$
\begin{equation*}
\mathscr{E}(x)=-\frac{q N_{D}}{\varepsilon_{s}}\left(x-x_{d}\right) \tag{E.1}
\end{equation*}
$$

for $0 \leq x \leq x_{d}$, and zero elsewhere. This result and the corresponding result for a $p$-type sample, are plotted in Fig. E. $1 c$ and $d$, respectively. Note that the peak field intensity occurs at the interface.

We next integrate the electric field to get the electrostatic potential profile. Noting that $\phi(x)$ is $\phi_{m}$ in the metal (i.e., for $x \leq 0$ ) and $\phi_{n}$ in the quasineutral region of an $n$-type semiconductor (i.e., for $x_{d} \leq x$ ), we obtain

$$
\phi(x)=\left\{\begin{array}{cl}
\phi_{m} & \text { for } x \leq 0  \tag{E.2}\\
\phi_{n}-\frac{q N_{D}}{2 \varepsilon_{s}}\left(x-x_{d}\right)^{2} & \text { for } 0 \leq x \leq x_{d} \\
\phi_{n} & \text { for } x_{d} \leq x
\end{array}\right.
$$

This result and the corresponding result for a $p$-type semiconductor are plotted in Fig. E. $1 e$ and $f$. Note in these illustrations of the field and potential that the electric field peaks at the interface and that the change in the potential occurs entirely within the semiconductor. The structure looks very much like a $p^{++}-n$ or an $n^{++}-p$ junction, with the metal playing the role of the heavily doped semiconductor. (As we shall see, however, there are important differences in other aspects of the device operation.)

To complete our model we need to find the depletion region width $x_{d}$ in terms of the total change in the electrostatic potential occurring inside the semiconductor. If we call this change the built-in potential and label it $\Delta \phi_{0}$, then


FIGURE E. 1
Net charge distribution, electric field profile, and electrostatic potential profile for a metal-semiconductor junction formed on an $n$-type semiconductor - (a), $(c)$, and (e), respectively - and on a p-type semiconductor-(b), $(d)$, and $(f)$, respectively-modeled using the depletion approximation.
we have

$$
\begin{equation*}
x_{d}(0) \approx \sqrt{\frac{2 \varepsilon_{s}\left|\Delta \phi_{o}\right|}{q N_{D}}} \tag{E.3}
\end{equation*}
$$

According to our model, $\Delta \phi_{o}$ is simply the difference in potential between the metal and the bulk of the semiconductor, $\phi_{m}-\phi_{n(o r p)}$, that is,

$$
\begin{equation*}
\Delta \phi_{o}=\phi_{m}-\phi_{n(\text { or } p)} \tag{E.4}
\end{equation*}
$$

In practice, however, it is often observed that this simple relationship between the built-in potential and the potentials in the metal and semiconductor does not hold and that the model we have been using has to be extended to include additional effects. Specifically, it is found that the surface of the semiconductor upon which the metal is placed has additional energy sites for electrons that are not found in the bulk of the material. These surface energy sites often fall within the range of energies corresponding to the energy gap in bulk material. A fraction of these states are filled by majority carriers, leading to a dipole layer on the surface comprised of the sheet of charge in the surface states and a depletion region extending into the bulk, as illustrated in Fig. E.2.

The sketch in Fig. E. 2 illustrates the net charge distribution up to a free semiconductor surface at $x=0$ for an $n$-type sample with a typical density of surface states in the energy gap. Notice that this dipole layer exists on any free semiconductor surface on which there are surface states and does not depend on a


FIGURE E. 2
Net charge distribution in the vicinity of the free surface of an $n$-type semiconductor sample with a typical density of surface states.
metal being present. If there were no surface states, there would be no depletion of the surface (i.e., the net charge would be zero up to the surface).

When a metal is put on this surface, the electrostatic potential profile and net charge distribution change to reflect both the difference in the electrostatic potential between the metal and the bulk of the semiconductor (as before) and now also the surface states on the semiconductor surface. Typical profiles are illustrated in Fig. E.3, which presents the same information as was presented earlier in Fig. E.1, but now for a situation in which there are also surface states. For this figure we see that the electric field and charge profiles in the semiconductor look pretty much the same as they did before, although at the interface there is an additional impulse of charge just inside the semiconductor (recall that the original impulse was just inside the metal) and there is now an impulse in the electric field. The potential profile in the semiconductor also has the same shape, but now there is a step change in potential at the interface between the semiconductor and the metal. Equation (E.2) describing $\phi(x)$ must be modified as follows:

$$
\phi(x)=\left\{\begin{array}{cl}
\phi_{m} & \text { for } x \leq 0 \\
\phi_{i} & \text { at } x=0^{+} \\
\phi_{n}-\frac{q N_{d}}{2 \varepsilon_{s}}\left(x-x_{d}\right)^{2} & \text { for } 0^{+}<x \leq x_{d} \\
\phi_{n} & \text { for } x_{d} \leq x
\end{array}\right.
$$

Thus the built-in potential in the semiconductor, $\Delta \phi_{0}$, is no longer given by Eq. (E.4); the step change, $\phi_{m}-\phi_{i}$, caused by the charge doublet at the interface has to be subtracted; thus

$$
\begin{equation*}
\Delta \phi_{0}=\phi_{i}-\phi_{n(\text { or } p)} \tag{E.4'}
\end{equation*}
$$

We can presumably extend our model to incorporate surface states and calculate the step change in the potential at the interface, but as a practical matter the problem of modeling the surface states and the interface in detail and relating the potential step to fundamental materials parameters has proven to be very difficult. A satisfactory, general model for the interface has yet to be developed. In practice, therefore, the built-in potential $\Delta \phi_{o}$ between a given metal and semiconductor is more often determined experimentally than theoretically. That is, we don't calculate it, we measure it.

To summarize our model for an unbiased metal-semiconductor ( m -s) junction, there is a dipole layer at an m-s junction formed by sheets of charge at the metal-semiconductor interface and a depletion region extending into the semiconductor surface.* The strength of the dipole and width of the depletion region

[^33]
(a)

(b)

(c)

FIGURE E. 3
Net charge distribution, electric field profile, and electrostatic potential profile for a metal-semiconductor junction formed on an $n$-type semiconductor $[(a),(b)$, and (c), respectively], modeled using the depletion approximation and assuming the existence of surface states.
$x_{d}$ depend on the built-in potential $\Delta \phi_{o}$, at the m-s junction through Eq. (E.3). The built-in potential is related to the electrostatic potential difference between the metal and the semiconductor and to the surface state density and distribution on the semiconductor surface. It is in general determined empirically for a given combination of metal, semiconductor, and fabrication process.

## E. 2 REVERSE BIASED METAL-SEMICONDUCTOR JUNCTIONS

When we form a metal-semiconductor junction on a moderately doped semiconductor and the built-in potential is on the order of 0.5 V or more, that junction will behave electrically much like a $p-n$ junction; that is, it will conduct relatively well for one polarity of bias (forward bias) and will block the current flow in the other polarity of bias (reverse bias). Assuming for now that we have such a junction and that we reverse-bias it by an amount $v_{m s}$, the main change to occur is that the electrostatic potential drop in the semiconductor will increase from $\Delta \phi_{o}$ to $\Delta \phi_{o}-v_{m s}$ and the depletion region width will increase to

$$
\begin{equation*}
x_{d}\left(v_{m s}\right) \cong \sqrt{\frac{2 \varepsilon_{s}\left|\Delta \phi_{o}-v_{m s}\right|}{q N_{d}}} \tag{E.5}
\end{equation*}
$$

This observation provides us with a means to measure $\Delta \phi_{o}$. As we saw with a $p-n$ junction, the small signal depletion capacitance of a reverse-biased junction is given by

$$
\begin{equation*}
C_{d p}=\frac{\varepsilon_{s} A}{w} \tag{E.6}
\end{equation*}
$$

which in this case becomes

$$
\begin{equation*}
C_{d p}\left(V_{M S}\right)=A \sqrt{\frac{\varepsilon_{s} q N_{d}}{2\left|\Delta \phi_{o}-V_{M S}\right|}} \tag{E.7}
\end{equation*}
$$

because $w$ is essentially $x_{d}$. Rewriting this as

$$
\begin{equation*}
\frac{1}{C_{d p}^{2}}=\frac{2\left(\Delta \phi_{o}-V_{M S}\right)}{\varepsilon_{s} q N_{d} A^{2}} \tag{E.8}
\end{equation*}
$$

gives us the result we want. We see clearly that if we measure $C_{d p}$ as a function of $V_{M S}$ and plot $\left(1 / C_{d p}\right)^{2}$ against $V_{M S}$, we should get a straight line whose intercept on the horizontal axis is $\Delta \phi_{o}$. Furthermore, from the slope of the line we can also determine the doping level in the semiconductor. Such a plot is called a C-V plot, and this procedure, illustrated in Fig. E.4, is an extremely common technique used to measure the doping level in semiconductor samples and is one of the primary ways of determining $\Delta \phi_{o}$.

## E.3. FORWARD BIAS AND CURRENTS

As we start the discussion of current flow across m-s junctions, a word of explanation is in order. Without developing models for the carrier populations and for


FIGURE E. 4
Illustration of how a typical C-V plot might appear. The slope of the remaining straight line is inversely proportional to the doping concentration of the semiconductor.
carrier flow in metals, we cannot be particularly quantitative; consequently the qualitative discussion to follow asks you to accept more facts on faith than do other parts of this text. Nonetheless, based on your knowledge of $p-n$ junctions, you should be able to understand the discussion and, hopefully, be comfortable with the results presented.

The first point to appreciate is that an m-s junction with a large built-in potential and wide depletion region, like those pictured in Fig. E. 1 and E.3, does behave electrically like a diode. When the bias is such that the built-in potential is lowered, then majority carriers in the semiconductor readily flow into the metal. There is no corresponding increase in the flow of charge carriers from the metal to the semiconductor, however, because it turns out that the barrier to carrier flow from the metal into the semiconductor is not affected significantly by the bias. This is one place where we need more detailed models for a metal to really explain what is going on, but you can perhaps understand this a little by realizing that essentially all of the potential drop is in the semiconductor and that the picture in the metal changes very little with bias. Thus in an m-s diode, the current that flows in forward bias consists almost exclusively of majority carriers moving from the semiconductor into the metal. In reverse bias there are very few minority carriers in the semiconductor to flow into the metal; the barrier in the metal changes very little, and few carriers flow from the metal into the semiconductor. The barrier at an m -s junction thus blocks carrier flow in reverse bias just as it does in a $p-n$ junction.

The second point to appreciate is that unlike the situation in a $p-n$ junction, the flow of carriers into the metal across an $\mathrm{m}-\mathrm{s}$ junction is not limited by minority carrier diffusion, the controlling process in a $p-n$ junction. Instead the current is limited by how readily the majority carriers in the semiconductor drift and diffuse across the space-charge layer (a process that happened so quickly in a $p-n$ junction compared to minority carrier diffusion that we neglected it) and by how fast the carriers move into the metal (a process called thermionic emission). Since these processes do not limit the carrier motion as much as diffusion, the carrier and charge fluxes (i.e., the current densities) are larger across an $\mathrm{m}-\mathrm{s}$ junction than
across a $p-n$ junction (assuming the same applied bias and similar doping levels). This difference in current densities between m-s and $p-n$ junctions is made even greater by the fact that the potential barrier the carriers must surmount (i.e., the built-in potential) is lower in an m-s junction than in a $p-n$ junction.

Quantitatively, the current across an m-s junction varies exponentially with the applied bias just as it does for a p-n junction. Thus we have, assuming for purposes of discussion an $n$-type semiconductor,

$$
\begin{equation*}
i_{D}=I_{S}\left(v_{\mathrm{AB}}\right)\left[e^{q v_{\mathrm{AB}} / k T}-1\right] \tag{E.9}
\end{equation*}
$$

This relationship is plotted for a representative device in Fig.E.5. The exponential behavior is a consequence of the fact that the number of carriers with enough energy to surmount the potential energy barrier varies exponentially with the height of the barrier (normalized to $k T$ ), just as was the case in a $p-n$ junction, and of the fact that the barrier height $\left(\Delta \phi_{o}-v_{A B}\right)$ varies linearly with the applied voltage $\nu_{A B}$.

We cannot model the saturation current $I_{S}$ without having modeled the metal in more detail, so we will limit ourselves here to general comments about it. As we have already stated, $I_{S}$ for an m -s junction is typically larger than the saturation current in a comparable $p-n$ diode.* This difference can amount to many orders


FIGURE E. 5
Current-voltage relationship for a representative metal-semiconductor diode (solid curve) plotted on the same axes as a comparable $p-n$ junction diode (dashed curve). Notice the larger forward and reverse currents in the $\mathrm{m}-\mathrm{s}$ diode and the lack of true current saturation in the reverse characteristic.

[^34]of magnitude, which translates to several tenths of a volt on the voltage scale, as illustrated in Fig. E.5. Also, there is a weak dependence of $I_{S}$ on the applied bias in an m-s junction. This factor is not noticeable in forward bias, where the exponential factor dominates, but it is evident in reverse bias as the absence of a true saturation of the reverse current, as illustrated in Fig. E.5. This feature is more of a curiosity than anything of any practical consequence, however.

Summarizing the key differences between $\mathrm{m}-\mathrm{s}$ and $p-n$ junctions, the most prominent feature is that an m -s junction has a larger forward current at a given forward bias than does a comparable $p-n$ diode. Furthermore, this current is comprised almost entirely of majority carriers from the semiconductor; there is typically negligible injection of excess minority carriers into the semiconductor from the metal. Both of these features (i.e., the larger forward current and the lack of minority carrier injection) are used to advantage in many of the applications of m -s junction as diodes (see Sec. E.4).

## E. 4 SCHOTTKY DIODES

Historically, rectifying metal-semiconductor junctions have been called Schottky diodes, after W. Schottky, the researcher who first correctly modeled the currentvoltage characteristics of these devices (previous models had predicted the opposite polarity for the rectification). More recently, the trend has been to call them simply metal-semiconductor, or $\mathrm{m}-\mathrm{s}$, diodes. As a rule of thumb, an $\mathrm{m}-\mathrm{s}$ junction with a barrier greater than 0.5 V and a depletion region at least $0.1 \mu \mathrm{~m}$ wide will show useful rectification at room temperature (i.e., will have terminal characteristics like those shown in Fig. E.5) and will be modeled well by Eq. (E.9).

Such m-s diodes find a number of applications. One of the most common is in the gate of a metal-semiconductor field effect transistor, or MESFET (see Sec. 10.3). In this application the m -s diode has the virtues that it is much easier to fabricate than a $p-n$ junction and that it can be made physically much smaller than a $p-n$ junction. It has also made it possible to fabricate FETs (and diodes, for that matter) in wide-bandgap semiconductors in which it is very difficult or even impossible to make a $p-n$ junction.

The MESFET application uses the m -s diode in reverse bias, but another important application uses this diode's unique forward characteristics. That application is in collector clamping. The idea is that when a bipolar transistor saturates, a large number of minority carriers are injected into the quasineutral region of the collector and the transistor cannot be switched out of saturation until these carriers are removed (see Chap. 16). This slows saturating logic circuits such as transistor-transistor logic (TTL) dramatically. One solution is to put an m-s diode in parallel with the base-collector diode. In the forward active region, when the base-collector junction is reverse-biased, so too is the m -s diode and nothing is changed by the diode's presence. In saturation, however, when the collector-base junction is forward biased, the m-s junction with its much larger current is the one that conducts; the collector-base $p-n$ junction never really turns on and so doesn't conduct. Consequently, there are no minority carriers injected into the collector


FIGURE E. 6
(a) Schematic representation of a Schottky clamped bipolar transistor; (b) the normal circuit symbol used to represent this device; (c) the cross-section of a typical realization of this device on a silicon substrate.
and the transistor can be switched out of saturation very quickly. The m-s junction itself switches very quickly because there is no minority carrier charge storage associated with it either, as we discussed in Sec. E.3. That is, the current through an m-s diode consists of carriers flowing into the metal. TTL logic that uses this concept is called Schottky-clamped TTL. A Schottky-clamped bipolar transistor, shown schematically in Figs. E. $6 a$ and $b$, is easily fabricated in silicon because aluminum deposited on the lightly doped $n$-type collector region forms a good m -s diode. The device cross section in Fig. E. $6 c$ illustrates how this might be implemented in practice. Note that the metal is patterned so as to simultaneously make an ohmic contact to the base and a rectifying contact to the collector. The same metal is patterned to make ohmic contact to the collector elsewhere on the device via the heavily doped $n^{+}$-region.

Other applications of m -s diodes also make use of the fact that there is no minority carrier injection associated with them and that they can therefore operate extremely quickly. This, coupled with the fact that they can be patterned in very small dimensions, has resulted in their wide use as high-frequency rectifiers. Very small-diameter m-s diodes are used in radio astronomy, for example, to rectify signals at hundreds and even thousands of gigahertz. Similarly, the fastest
photodetectors are specially designed m -s diodes. The speed, simplicity, and size of m -s diodes make them extremely important devices in modern electronics. They are some of the fastest semiconductor devices ever made.

## E. 5 OHMIC CONTACTS

In m-s junctions in which the built-in potential is only a few tenths of a volt, the saturation current $I_{s}$ will be so large that there is very little useful rectification. The resistance to current flow presented by the potential barrier at the metal-semiconductor interface is little more than that found in the bulk of the semiconductor.

This effect is further enhanced if the semiconductor is more heavily doped. What little depletion there is at the surface is then very shallow, and the surface field is relatively high. This, coupled with a phenomenon called the image force potential, serves to actually lower the potential barrier even further. Such an m-s junction can easily function as a low-resistance ohmic contact. The contact made by aluminum to the $p$-type base region of a bipolar transistor is an example of this type of contact.

In many cases we need to make ohmic contacts and cannot use metals that form m -s junctions with small built-in potentials. Aluminum on $n$-type silicon is just one such situation. Aluminum is a very nice metal to use for many reasons it is a good conductor, it is inexpensive, it is easily etched and patterned, it is fairly inert, and it adheres well to silicon and to silicon dioxide-but it yields a large built-in potential on $n$-type silicon. To overcome this problem, we must very heavily dope the silicon under the aluminum when we want an ohmic contact with aluminum to $n$-type silicon. This results in a depletion region at the metalsemiconductor interface that is very, very narrow, and two things happen. First, because of image force lowering, the height of the potential barrier is reduced somewhat. Second, and more importantly, we find that the carriers can tunnel right through the very thin barrier. Tunneling is a quantum mechanical phenomenon that describes the fact that there is a finite probability that a particle can penetrate any potential energy barrier. If the barrier is thin enough and/or low enough, the probability of penetration can be very high and, in the case of an m-s junction, there will be negligible resistance to current flow and the contact will look ohmic. This is the way ohmic contact is made to the collector and emitter regions of an $n p n$ silicon BJT.

For many semiconductors it is common practice to make ohmic contacts by depositing on the surface an alloy that contains a suitable dopant, say zinc in the case of p-type GaAs, along with the primary contact metal, say gold. The structure is then heated to diffuse some of the dopant into the semiconductor to produce a very heavily doped region under the metal. As we have just said, the corresponding depletion region at the m -s interface is very narrow in such a situation and can easily be tunneled by the charge carriers. The result is a low-resistance "alloyed" ohmic contact.

## APPENDIX F

## LARGE- AND SMALL-SIGNAL VALUES OF $\beta$

In our models for bipolar junction transistors, two different common-emitter forward current gains $\beta$ have been introduced. There is the large-signal current gain, which is given an uppercase $F$ subscript and is defined as

$$
\begin{equation*}
\beta_{F}=\frac{I_{C}}{I_{B}} \tag{F.1}
\end{equation*}
$$

and there is the small-signal, or incremental, current gain, which is given a lowercase $f$ subscript and is defined as

$$
\begin{equation*}
\beta_{f}=\frac{\partial i_{c}}{\partial i_{b}} \tag{F.2}
\end{equation*}
$$

In the operating regions where a given bipolar transistor is accurately modeled by the Ebers-Moll model, these two $\beta$ are identically equal and we need not be concerned about distinguishing between them. In other regions of operation such as those corresponding to very low and very high collector current operation, for example, effects not included in the Ebers-Moll model tend to become important; these effects can lead to significant differences in these two expressions for $\beta$. Seeing how this is treated in practice can give us some useful lessons in modeling.

Since the effects that we have neglected in the Ebers-Moll model-such as excess recombination in the emitter-base junction, series resistance in the base, and base-width modulation-arise initially as small effects, we are usually able to ignore them in our large-signal modeling much longer than we can in our small-signal analyses. A picture that might help you visualize this is to think first of a region of operation in which the Ebers-Moll model is adequate for both large-
and small-signal operation; this region, which strictly speaking is the only place we would try to use the Ebers-Moll model, is depicted schematically in Fig. F. 1 as region A. It is a natural desire, however, to want to use our models over as wide a range as possible, and if we can stretch things a bit, as it were, so much the better. As we consider using the Ebers-Moll model outside of this strictly valid region, we tend to find that the first parameters to "feel" this change (i.e., to be affected by the inadequacy of the model) are the incremental parameters (e.g., $\beta_{f}$ ) whereas the large-scale parameters, such as $\beta_{F}$, are initially much less affected. This should intuitively seem very reasonable. If you are initially on a large flat plateau and begin to move off this plateau, the first thing you will sense in doing so will be the downward (or upward) slope of the edge. You will sense this slope long before you have actually moved down (or up) much at all on an absolute scale.

There is thus typically a boundary region around the central "ideal" region (see Fig. F.1) where, in the case of a bipolar junction transistor, the Ebers-Moll model is useful and reasonably accurate for large-signal calculations even if it neglects certain effects, while at the same time the presence of these effects must be acknowledged and included in the small-signal model. Eventually we find ourselves in an operating region where the effects we neglected initially are so important that they cannot be ignored in the large-signal model either, but until that point we use the Ebers-Moll model for large-signal modeling and we need to adjust only the incremental model by, for example, replacing $\beta_{F}$ with $\beta_{f}$, adding $r_{x}$ to the base lead, putting $g_{0}$ across the output, inserting $C_{\pi}$ and $C_{\mu}$, etc.

When you are faced with a problem in which the large-signal and smallsignal $\beta$ terms differ, you can usually decide which $\beta$ to use in a particular situation fairly easily. There is at least one situation, however, that may be more confusing but can also be very instructive to consider in more detail: the relationship between $g_{\pi}$ and $g_{m}$ in the hybrid- $\pi$ model.


FIGURE F. 1
Illustration of the operating variable space for a model depicting regions $A$, where large-signal and small-signal models based on the same description hold; B , where the large-signal model is adequate but where additional effects need to be incorporated into the small-signal model; and C, where both models must acknowledge the presence of effects not considered in the original model.

We specified in Sec. 8.2.2a that $g_{m}$ is the more fundamental of these quantities and is given by $q\left|I_{C}\right| / k T$. We also said that the incremental input conductance $g_{\pi}$ is to be determined from $g_{m}$ as $g_{m} / \beta_{f}$, where the small-signal $\beta$ is to be used. This last point seems perfectly reasonable, but you might just as well consider it equally reasonable to start with the base-emitter diode and say that the incremental input conductance $g_{\pi}$ is $q\left|I_{B}\right| / k T$, which, since $I_{B}=I_{C} / \beta_{F}$, says now that $g_{\pi}$ is $g_{m} / \beta_{F}$. This is not what we said above. Which is it, $\beta_{f}$ or $\beta_{F}$ ?

The answer is $\beta_{f}$, but to understand why, we need to look at what is going on physically. We will consider the case of small currents, where base-emitter recombination becomes important. The Ebers--Moll model neglects the excess recombination component of the emitter-base junction current; to include this current in our model we will add a new element in parallel with the emitterbase junction, as illustrated in Fig. F.2. Since we are discussing the issue in the context of the hybrid- $\pi$ model, a common-emitter configuration, we will focus on the large-signal model in Fig. F. $2 b$, which is the more convenient one for analyses of common-emitter topologies. In both Fig. $2 a$ and $b$, a nonlinear element representing the excess junction current has been inserted across the emitter and base terminals and in parallel with the ideal exponential base-emitter junction diode (this element is the same in both representations). Notice in Fig. F. $2 b$ that we have used $B_{F}$ rather than $\beta_{F}$ for the current gain of the Ebers-Moll transistor to avoid introducing yet another current gain labeled $\beta$. When excess recombination (i.e., the shunting element) can be neglected, all of these current gains ( $B_{F}, \beta_{F}$, and $\beta_{f}$ ) are identical; in general, though, all three are different.

We next find an incremental equivalent circuit for the model in Fig. F.2b; this is illustrated in Fig. F.2c. The new elements in this model have the following definitions: The conductance of the nonlinear element representing the excess currents is simply

$$
\begin{equation*}
g_{b n}=\left.\frac{\partial i_{B N}}{\partial v_{B E}}\right|_{Q} \tag{F.3}
\end{equation*}
$$

We will not specify it further. The conductance of the exponential diode is

$$
\begin{equation*}
g_{b i} \equiv \frac{q I_{B I}}{k T} \tag{F.4}
\end{equation*}
$$

and since both derive from the Ebers-Moll model, the transconductance $g_{m}$ must be related to $g_{b i}$ as follows:

$$
\begin{equation*}
g_{m}=B_{F} g_{b i} \tag{F.5a}
\end{equation*}
$$

Using Eq. (F.4), we find that this becomes

$$
\begin{equation*}
g_{m}=\frac{q B_{F} I_{B I}}{k T} \tag{F.5b}
\end{equation*}
$$

which, referring to Fig. F. $2 b$, can be written as

$$
\begin{equation*}
g_{m}=\frac{q I_{C}}{k T} \tag{F.5c}
\end{equation*}
$$



FIGURE F. 2
( $a$ and $b$ ) Common-base and common-emitter large signal Ebers-Moll bipolar transistor models, respectively, with a nonlinear element (NLE) added to represent excess low-level recombination at the emitter-base junction; (c) an incremental equivalent circuit for the large-signal model in (b); (d) the mid-band hybrid- $\pi$ model.
since $I_{C}$ is $B_{F} I_{B I}$. So our first result is that $g_{m}$ is still given by the same expression, $q I_{C} / k T$, even in the presence of excess junction recombination.

Now we turn to the input conductance, which we call $g_{\pi}$ in the hybrid$\pi$ model, Fig. F. $2 d$. Now the input conductance is $g_{b n}$ in parallel with $g_{b i}$, so $g_{\pi}=g_{b n} \| g_{b i}$. This expression does not help us much, however, since we don't know anything about $g_{b n}$. In fact, we would like to avoid altogether having to develop a model for the nonlinear shunting element, if at all possible.

To be able to proceed, we first note that $g_{\pi}$ can also be written as $\partial i_{b} / \partial v_{\pi}$. Since $\beta_{f}$ is $\partial i_{c} / \partial i_{b}$ and $g_{m}$ is $\partial i_{c} / \partial v_{\pi}$, we should be able to relate $g_{\pi}$ to $g_{m}$, which we know, and $\beta_{f}$, which we can easily measure using the sum rule of differential equations. Specifically, then, we start with

$$
g_{\pi}=\frac{\partial i_{b}}{\partial v_{\pi}}
$$

Viewing $i_{b}$ as a function of $i_{c}$ and $v_{c e}$, we can write this as

$$
\begin{equation*}
g_{\pi}=\frac{\partial i_{b}}{\partial i_{c}} \frac{\partial i_{c}}{\partial v_{\pi}}+\frac{\partial i_{b}}{v_{c e}} \frac{\partial v_{c e}}{\partial v_{\pi}} \tag{F.6}
\end{equation*}
$$

However, the last term is negligible since the current $i_{b}$ does not depend on the collector-emitter voltage. Thus after recognizing $\beta_{f}$ and $g_{m}$ in Eq. (F.6), we have

$$
\begin{equation*}
g_{\pi}=\frac{g_{m}}{\beta_{f}} \tag{F.7}
\end{equation*}
$$

It is clearly $\beta_{f}$ that enters here, as we said earlier was the case.
We have skirted the issue of modeling or otherwise specifying the characteristics of the shunting element in our schematics. You realize, of course, that it is present through $\beta_{f}$ in our model at this stage. We can measure $\beta_{f}$, and we can determine what $g_{b i}$ is, so it is actually possible to extract $g_{b n}$ from data, but this is not usually done. Instead, we normally study deviations from ideality in the base emitter junction through large-signal plots of $\log I_{C}$ and $\log I_{B}$ versus $V_{B E}$. Such a plot, called a Gummel plot, is a very powerful and widely used analytical tool for studying low-level junction currents in transistors.

## APPENDIX $G$

## INTEGRATEDCIRCUIT FABRICATION

Manufacturing the microelectronic devices and integrated circuits studied in this text involves a fascinating mix of many disciplines of science and engineering. We will have room for only a brief exposure in this appendix, but even then you should start to see both the power and beauty of the vast array of fabrication technologies that have been developed to produce semiconductor electronics. These technologies drive the microelectronics revolution that has been proceeding unabated since the 1960 s and has continued to evolve at a hectic pace. Some of you may well want to make this area a major focus of your career.

In this appendix we will first look from a general perspective at the variety of technologies used to fabricate devices and circuits. After this overview of the device engineer's technological toolbox, we will look step-by-step at the processing sequences followed to realize several representative integrated circuits. Specifically, we will look at the fabrication of junction isolated bipolar ICs, at $n$-MOS, at CMOS and BiCMOS, and at refractory-metal-gate MESFET logic.

## G. 1 ELEMENTS OF SEMICONDUCTOR PROCESSING

There are certain process technologies that are intrinsic to all semiconductor fabrication. These include crystal growth, doping, encapsulation, microlithography, metallization, and etching and cleaning. We will look at each in turn in this section.

## G.1.1 Crystal Growth

Most microelectronic processing begins with a single crystal semiconductor disk called a wafer. This wafer is the foundation upon which the device or circuit is built and as such is called the substrate. Wafers are cut from long cylindrical crystals called boules using special high-speed saws with very thin blades to minimize kerf loss. They are then polished on one side, first mechanically and then chemically, to yield a flat, damage-free surface. The wafers are made only as thick as necessary for them to have sufficient mechanical strength that they do not break during processing; making them thicker only wastes valuable material. As a consequence, GaAs wafers are thicker than the same-diameter Si wafers, because GaAs is more brittle. A typical wafer of either material is on the order of half a millimeter thick (e.g., 0.4 to 0.6 mm , or 400 to $600 \mu \mathrm{~m}$ ). A boule and a wafer cut from a boule are illustrated in Fig. G. $1 a$ and $b$, respectively.

The "bulk" crystal growth technology used to produce boules of silicon and other semiconductors ( $\mathrm{Ge}, \mathrm{GaAs}, \mathrm{GaP}$, InP, etc.) has developed over the years to the point that it is possible to produce bulk single crystals of exceptional purity (less than $10^{12}$ unintentional electrically active impurities per $\mathrm{cm}^{3}$ ), perfection (less than 10 defects per $\mathrm{cm}^{2}$ on any cross section), and size (up to 30 cm in diameter and 1 m in length). The standard wafer diameter used in processing tends to increase with each generation of technological improvements and equipment because the economics of the business favors larger wafers. At present, most Si processing is done using 6 in . or 8 in . wafers, whereas GaAs and InP process lines use 3 in . or 4 in . wafers.


FIGURE G. 1
(a) Single crystal boule; (b) a single wafer cut from a boule like the one shown in (a); (c) cross-sectional sketch near the upper surface of a wafer upon which a thin epitaxial layer has been grown.

Almost as important as the growth and preparation of bulk crystals for substrates is the growth of thin crystalline layers on these substrates. In this process, which is called epitaxy, the wafer surface provides the template, or seed, for continued crystal growth. The growth is usually relatively thin (it is measured in microns) and usually differs from the substrate in terms of its doping level and perhaps even composition (in which case it would be called heteroepitaxy); an example is shown in Fig. G.1c. The epitaxial layer need not be uniform in doping or composition, of course, and many advanced research devices incorporate doping and/or composition profiles that are controlled with atomic-layer precision.

Most silicon epitaxy is done in a growth chamber, or reactor, in which the silicon wafers are heated to a temperature in the vicinity of $1000^{\circ} \mathrm{C}$ and exposed to a gas stream containing silicon tetrahydride (silane) and hydrogen. The silane decomposes near the heated substrate, depositing silicon on it; that is,

$$
\begin{equation*}
\mathrm{SiH}_{4} \xrightarrow{\Delta} \mathrm{Si} \downarrow+2 \mathrm{H}_{2} \uparrow \tag{G.1}
\end{equation*}
$$

If the deposition occurs slowly enough and the temperature is high enough that the depositing silicon atoms can move about and find their energetically favored crystal lattice sites, the layer that is formed will be a single crystalline continuation of the substrate. This process is called chemical vapor deposition (CVD) or gasphase epitaxy. A typical reactor used for this type of growth is illustrated in Fig. G. 2.

Epitaxy can also be accomplished through solidification from a solution (liquid-phase epitaxy, LPE) or by direct condensation from a beam of atoms and/or molecules in a vacuum (molecular-beam epitaxy, MBE). LPE is widely used, for example, to produce gallium phosphide light-emitting diodes and gallium arsenide-based and indium phosphide-based laser diodes. MBE is used for many high-speed gallium arsenide field effect transistors and some laser diodes.

Epitaxial structures that incorporate layers with different compositions (but essentially the same lattice constant) are called heterostructures. III-V semiconductor devices have traditionally made wide use of heterostructures grown by LPE, MBE, and/or CVD. Most silicon integrated circuits using epitaxial layers


FIGURE G. 2
Representative chemical vapor deposition system for epitaxial growth of silicon.
simply use silicon epilayers, but heterostructures involving alloys of silicon and germanium also exist. Heterostructures that mix different families of semiconductors (elemental, III-V, II-VI, etc.) as well as insulators and metals have proven very difficult to realize, and perfecting them remains a research dream.

## G.1.2 Doping

Doping is the introduction of dopants into a semiconductor in a controlled manner. There are three common ways in which this is done: during crystal growth, by solid-state diffusion, and through ion implantation.

Bulk crystals are doped as they are grown by adding a controlled amount of dopant to the molten semiconductor as the crystal is being formed. A great deal of attention must be paid to ensuring that the doping is uniform across the diameter of a boule and from end to end. Variations of only a few percent can be tolerated. Doping during epitaxy is also accomplished by adding controlled amounts of dopants to the source solution, gas stream, or molecular beam. In the case of silicon CVD, for example, this might involve the addition of dopant hydrides such as diborane, phosphine, or arsine to the silane and hydrogen mixture. Again the control of the doping level and its uniformity across a wafer is a key processing issue.

Doping by solid-state diffusion involves establishing an elevated concentration of the desired dopant around a wafer (which is being held at a high temperature) and letting the dopant diffuse into the surface. By controlling the concentration of dopant in the ambient atmosphere, the temperature of the wafer, and the time of exposure, the amount of dopant introduced and its profile can be controlled.

A typical diffusion doping process involves two stages. In the first stage, called predeposition, a shallow doping profile having a very high surface concentration is created. The surface concentration after this step may be too high to be useful in a device, but it turns out that such high surface concentrations can at least be reproducibly established since they represent "saturation" levels. Thus this represents a very practical way of controlling the total amount of dopant introduced, even if it isn't all located exactly where we want it. In the second stage, called the drive, the exterior source of dopant is removed and the dopant left in the wafer after the first step is allowed to diffuse deeper into the wafer; at the same time the surface concentration decreases. (If a heavy surface concentration is desirable, the second step can be eliminated.) The dopant profiles corresponding to these two procedures are illustrated in Figs.G. $3 a$ and $b$, respectively. Notice that in the first type of diffusion, Fig.G. $3 a$, the profiles have roughly a complementary error function shape, whereas in the second, Fig. G. $3 b$, the profile is Gaussian. Both profiles are their maximum at the surface and have exponential tails.

To get a large dopant concentration in a wafer and to have the dopant diffuse in a useful distance within a practical length of time, the wafer must be relatively hot. A typical predeposition step in silicon might be done at 900 to $1000^{\circ} \mathrm{C}$ and last for tens of minutes; a typical drive step is done at an even higher temperature, say $1100^{\circ} \mathrm{C}$, for upwards of an hour or more. The resulting junction depth will be measured in microns (i.e., 1 to $10 \mu \mathrm{~m}$ ).


FIGURE G. 3
Doping profiles created by diffusion and ion implantation: (a) a constant surface concentration diffusion profile like that used for predepositoin; (b) a constant total dopant diffusion profile; and ( $c$ ) a typical ion implanted dopant profile.

The second post-growth doping process, ion implantation, begins by first stripping electrons off the desired dopant atoms to produce ions. A broad beam of these ions is accelerated through a large potential difference, say 100 kV , and is directed at the wafer surface. The impinging high-energy ions penetrate the wafer surface a fraction of a micron or more, depending on the accelerating voltage and the particular ion and semiconductor being implanted. The resulting profile is roughly Gaussian with the peak occurring in from the surface, as illustrated in Fig. G.3c. A major attraction of ion implantation is the amount of control that can be achieved over this profile, particularly at low doping levels and for relatively shallow junction depths.

A problem with ion implantation is that it creates a great deal of damage in the crystal. The atoms in the crystal lattice are, after all, what stop the impinging ions, and many of the lattice atoms are literally knocked out of position. To repair this damage and to encourage the implanted dopant atoms to occupy lattice sites themselves, a wafer is usually annealed (i.e., held at an elevated temperature for a period of time). The time and temperature of this annealing process are chosen to be long and high enough to promote the desired healing but not so long and high as to lead to appreciable diffusion of the implanted atoms.

In contrast to doping during bulk or epitaxial crystal growth, solid-state diffusion and ion implantation offer ways of selectively doping a semiconductor wafer in patterned areas or regions. This is particularly easy to do with ion implantation because it can be done simply by putting a polymer or metal film that is a few microns thick on the wafer surface and patterning it using the microlithography techniques we will discuss in the next section. The film, which blocks the impinging ions during the implantation sequence, is then removed before the postimplant anneal.

Doing a patterned diffusion is somewhat more difficult since diffusion occurs at such a high temperature. The layer that is used to block the dopant must be able to withstand these temperatures, must be an effective diffusion barrier, and must be easily patterned before diffusion and easily removed, if necessary, after. Two excellent choices for barrier materials are silicon dioxide, $\mathrm{SiO}_{2}$, and
silicon nitride, $\mathrm{Si}_{3} \mathrm{~N}_{4}$. Of these, the former is by far the most widely used. It is easily formed, especially when the semiconductor being processed is silicon, as we shall discuss in the next section.

An important difference between a doped region formed by ion implantation and one formed by diffusion comes about because diffused dopants will move laterally under a patterned diffusion barrier, going sideways almost as far as they go into the surface. Implanted dopants, on the other hand, do not spread laterally to any appreciable extent, and their shape is well defined by the edges of the pattern. This difference is illustrated in Fig. G.4.

## G.1.3 Encapsulation

Encapsulation refers to the formation of a protective layer on a wafer surface. Such a layer might be used to protect the wafer from dopants during diffusion or ion implantation, to protect and insulate the wafer from metal lines formed to connect the devices in a monolithic integrated circuit (and to insulate these metal lines from one another), to protect the exposed edges of $p-n$ junctions formed in the wafer from shorting due to contamination, and/or to simply shield the wafer from its environment.

It is particularly easy to form such an encapsulating layer on a silicon wafer by simply placing it in an oxidizing ambient at an elevated temperature. A tough, durable, and contiguous film of amorphous silicon dioxide, $\mathrm{SiO}_{2}$, forms over the entire surface. $\mathrm{SiO}_{2}$ is an excellent insulator and dielectric, and it is also impervious to most acids and solvents. At the same time, it is easily etched by hydrofluoric acid, HF, a dangerous but relatively easily handled acid that in dilute form will only very slowly attack most plastics and organic polymers. This is significant because although the $\mathrm{SiO}_{2}$ film that forms on the silicon surface is durable, it can be easily removed selectively using a combination of HF and a polymer film that has been patterned as desired to protect certain regions. This patterning process will be described in the next subsection on microlithography.


FIGURE G. 4
Vertical doping profiles at the edges of a patterned $p$-doped region created in an $n$-type wafer: (a) by diffusion; (b) by ion implantation. Note that the position of the junction is used to indicate the extent of the doping profile.

The $\mathrm{SiO}_{2}$ film, which is typically a few thousand angstroms thick, is transparent, although it appears to the observer to be colored because of optical interference. Different thicknesses display different colors. The situation is analogous to what is seen when there is a thin film of oil on a puddle of water. The result is very colorful in both cases.

Silicon dioxide forms on silicon when either oxygen or $\mathrm{OH}^{-}$ions diffuse through any $\mathrm{SiO}_{2}$ already on the surface and react with Si at the $\mathrm{SiO}_{2}-\mathrm{Si}$ interface. Thus as oxidation proceeds, the original silicon surface is consumed and a new, clean $\mathrm{SiO}_{2}-\mathrm{Si}$ interface is continually re-formed.

In addition to being a good insulator and a good protective layer, $\mathrm{SiO}_{2}$ is also a good diffusion barrier for many common $n$ - and $p$-type dopants, as we mentioned in the earlier subsection on doping. The use of $\mathrm{SiO}_{2}$ to block the diffusion of dopants is one of the most important uses of $\mathrm{SiO}_{2}$ in microelectronic device and integrated-circuit processing.

Silicon and silicon dioxide form a rather unique combination of materials. No other semiconductor forms a comparable durable, chemical-resistant, insulating film in this fashion, nor is there another film like it that forms on silicon. Silicon nitride, $\mathrm{Si}_{3} \mathrm{~N}_{4}$, is another excellent encapsulant material, for example, yet it is very difficult to nitridize silicon, and it is not possible to form thick $\mathrm{Si}_{3} \mathrm{~N}_{4}$ layers on silicon in the same way that $\mathrm{SiO}_{2}$ layers can be formed. The problem is that neither silicon nor nitrogen diffuse through $\mathrm{Si}_{3} \mathrm{~N}_{4}$, so the reaction quickly stops after a thin layer forms. The only way to form a thick $\mathrm{Si}_{3} \mathrm{~N}_{4}$ layer on silicon is by chemical vapor deposition, employing a reaction such as

$$
\begin{equation*}
3 \mathrm{SiH}_{4}+4 \mathrm{NH}_{3} \xrightarrow{\Delta} \mathrm{Si}_{3} \mathrm{~N}_{4} \downarrow+12 \mathrm{H}_{2} \tag{G.2}
\end{equation*}
$$

The reason it might be interesting to have silicon nitride available to use in a silicon process is that $\mathrm{Si}_{3} \mathrm{~N}_{4}$ is a diffusion barrier to oxygen also. Thus it can be used to block oxidation in selected regions on a silicon wafer.

Silicon dioxide and silicon nitride are also widely used in the processing of semiconductors other than silicon, and chemical vapor deposition is often used to form them. The reaction of Eq.(G.2) is used to produce $\mathrm{Si}_{3} \mathrm{~N}_{4}$ films, and $\mathrm{SiO}_{2}$ is obtained in a similar manner using a reaction such as

$$
\begin{equation*}
\mathrm{SiH}_{4}+2 \mathrm{O}_{2} \xrightarrow{\Delta} \mathrm{SiO}_{2} \downarrow+2 \mathrm{H}_{2} \mathrm{O} \uparrow \tag{G.3}
\end{equation*}
$$

Alternatively, it is also possible to create films of $\mathrm{SiO}_{2}, \mathrm{Si}_{3} \mathrm{~N}_{4}$, and other inorganic encapsulants (e.g., $\mathrm{Al}_{2} \mathrm{O}_{3}$ ), by a process called sputter deposition. The sample to be coated and a disk of the desired encapsulant material are placed facing each other in an evacuated vacuum chamber. The surface of the disk is then bombarded with high-energy argon ions, knocking some of its molecules off. If things are positioned correctly, these freed molecules will deposit on the sample surface, building up the desired encapsulating film. A major problem with sputter deposition is that the ions present can create damage on the semiconductor surface, which can be detrimental to device performance.
$\mathrm{SiO}_{2}$ and $\mathrm{Si}_{3} \mathrm{~N}_{4}$ are both materials that can withstand elevated temperatures, and they thus can be present during high temperature processing steps (i.e.,
diffusion, oxidation, annealing, etc.). There are other useful films (mostly organic in nature) that cannot withstand high temperatures and thus must be used only at later stages of processing (i.e., after the last high-temperature step). These materials (polyimide is a common example) are often used to build up a relatively thick encapsulating cover over a wafer and to separate multiple layers of interconnect metals. These layers can easily be several microns thick, whereas the $\mathrm{SiO}_{2}$ and $\mathrm{Si}_{3} \mathrm{~N}_{4}$ layers mentioned earlier tend to be only a few tenths of a micron thick.

## G.1.4 Microlithography

The patterning that has been mentioned in previous sections is accomplished by applying a light-sensitive organic polymer to the surface of the wafer, thereby converting it into, if you will, a photographic plate. This organic substance, called resist or, if it is light-sensitive, photoresist, is applied as a liquid to the top surface of a spinning wafer so that it forms a uniform thin film roughly a micron thick over the entire surface. (The exact thickness depends on the viscosity of the liquid and the rate of rotation.) After the coated wafer is heated briefly to dry and set the film, it is ready to be exposed in the desired pattern. Some photoresists, called positive resists, are depolymerized by light so that regions are exposed to illumination will be removed when the resist is subsequently developed. Other resists, negative resists, are polymerized by light, and it is the unexposed areas that are removed during developing. In either case, the developed wafer is left with certain regions protected by a photoresist film, and other regions bare. Consequently, by using suitable etchants, pre-existing metallic and/or dielectric layers on the wafer surface, or even some of the semiconductor itself, can be etched away in the open areas. Once the desired etching has been accomplished, the photoresist layer can itself be selectively removed using organic solvents, which do not affect the underlying structures. As an example of this type of processing, the use of this technique to etch an opening in a silicon dioxide layer on a silicon wafer is illustrated in Fig. G.5.

The exposure of a desired pattern in photoresist on a wafer and the alignment of that pattern to a pre-existing pattern already on the wafer surface can be accomplished in several ways. Most commonly, a glass plate, called a mask, that contains the desired pattern is first prepared. A typical mask is illustrated in Fig. G.6. Making such a mask is itself a major challenge because the pattern on it may contain upwards of a million rectangles, many with submicron widths and spacings, and it must be perfect.

An important point to realize in looking at the mask in Fig. G. 6 is that each wafer processed will contain many circuits. These circuits will eventually be cut apart, but they are kept together and processed simultaneously as long as possible, typically until the time comes to package them individually. This ability to process many circuits at once and thus to share the cost of processing an individual wafer among many chips significantly reduces the cost per chip and is a major factor in the economics of the integrated-circuit industry. Equally important is the possibility at many stages of the processing to process many wafers simultaneously. As we shall see shortly, this is not possible in photolithography, but


FIGURE G. 5
Etching an opening in a $\mathrm{SiO}_{2}$ film on a Si surface photolithographically: (a) the oxidized silicon wafer; (b) the same wafer coated with photoresist; (c) exposure of the photoresist to the mask pattern; (d) after development of the resist; (e) after etching; $(f)$ after removal of the resist.
other processes such as diffusion and chemical vapor deposition can be performed on batches of 25 to 50 wafers at a time.

The pattern on a mask is transferred onto a photoresist-coated wafer on an instrument called a mask aligner. An aligner first lets its operator align the pattern on a mask with any pattern already on the wafer, and then it exposes the resist to light. In some aligners, called contact aligners, the mask and wafer are brought into actual contact and pressed together during the exposure cycle. If the two can be brought into perfect contact, this technique will replicate extremely small patterns. In practice, perfect contact is difficult to achieve, so this technique is primarily used where feature sizes exceed $1 \mu \mathrm{~m}$. Contact printing is also very hard on both wafers and masks. A gentler alternative is to simply bring the mask and wafer into close proximity and do the exposure using a highly columnated light beam. More common than such proximity aligners, however, are projection aligners, which actually project the image on the mask through a lens and onto the wafer


FIGURE G. 6
Perspective view of a mask used in photolithography.
surface. These aligners have the additional advantage that the mask image can be larger than the ultimate device size (typically by factors of 5 or 10 times) because the projection need not be one-to-one; furthermore, the mask needs to contain only one of the patterns to be repeated over the wafer surface because a projection aligner can itself easily do mulitiple exposures, stepping and repeating the pattern across the wafer at this stage of the processing. This allows a certain degree of flexibility in the processing as well, since patterns can be different in the various cells if that is desired.

As modern integrated circuits and microelectronic devices have been pushed to smaller and smaller dimensions, the limits of optical lithography techniques imposed by the wavelength of light have led to the extension of optical systems to vacuum ultraviolet operation and, more fundamentally, to the development of still other lithography techniques. The two most successful such techniques use, respectively, x-rays and electrons to expose a pattern in resist.

X-ray lithography is conceptually identical to optical proximity lithography and differs mechanically only in such details as the nature of the mask (a thin membrane rather than a piece of glass), the composition of the resist (one sensitive to x-rays rather than light), and the radiation source (a syncrotron or other intense x -ray source rather than a lamp). The x -rays used have a wavelength on the order of a few angstroms, however, rather than a few thousand angstroms, so the resolution potential of x-ray lithography is correspondingly orders of magnitude greater than that of optical lithography.

Electron-beam (e-beam) lithography involves an entirely different approach. In this technique, a fine beam of electrons is used to write the desired pattern directly into the resist. The image is re-created on every wafer, so this process is relatively slow, but by the same token, every device or circuit can be individually tailored (i.e., customized) if that is of interest. In practice what is often done is that a mixture is used of optical lithography for the large portions of the pattern and e-beam lithography for the critical small-dimension elements. Since the latter typically represents but a tiny fraction of the total pattern, this approach can result in dramatic savings in processing time and expense with no loss in product performance. E-beam lithography is also often used to generate mask patterns for X-ray lithography and for vacuum ultraviolet optical lithography.

## G.1.5 Metallization

Contact is made where necessary to the various doped regions in a wafer, and the various devices on the wafer are interconnected electrically, by etching openings through any dielectric layers that cover the wafer, depositing a thin metallic film on the wafer surface, and then etching the metal into the desired wiring pattern. Alternatively, after the contact holes have been etched through the dielectric, resist can be put on the wafer and patterned so as to remove it where metal is desired; a metallic film is then deposited over the wafer, and the resist is removed. If care has been taken to produce a thick resist pattern with vertical, or even retrograde, sidewalls so that the metal film is discontinuous over the edges of the pattern, the resist will lift the metal off with it as it is removed. This procedure, called lift-off, is particularly useful with metals such as gold that are troublesome to etch and when very fine metal patterns are sought. These two procedures for producing metal contacts and interconnect patterns are illustrated in Fig. G.7.

Vacuum deposition techniques are most commonly used to coat a wafer with a metallic film. The simplest such technique is called thermal evaporation. In this technique, the wafer to be coated is placed in a vacuum chamber, which can be evacuated to a pressure below $10^{-6}$ torr, along with a source of the metal of interest, which is itself in a vessel in which it can be heated to boiling. The idea is that when the metal is brought to boiling, atoms gain enough thermal energy to leave the metal and travel in the vacuum until they collide with a cold surface and condense. If the wafer is positioned so that an appreciable number of these escaping atoms condense on its surface, the desired metallic thin film is obtained. If we want a metallic film that is an alloy and/or is comprised of several layers of different metals, multiple source vessels can be provided inside the vacuum chamber.

Certain metals have extremely low vapor pressures and do not evaporate except at extremely high temperatures, so simple thermal evaporation of the metals is impractical because no vessel can contain them. Sometimes, such metals can be electron-beam evaporated. In this technique an intense electron beam is directed at the surface of a pellet of metal, producing a very localized, extremely hot molten puddle of the metal in the large pellet. The metal serves as its own vessel and thus is not contaminated in the process.
(a)


(c)

(b)

(d)

FIGURE G. 7
Two methods of patterning metal films: ( $a$ and $c$ ) the lift-off process; ( $b$ and $d$ ) the use of photoresist as an etch mask. In (a), the photoresist has been spun-on, exposed, and developed and metal has been deposited over the wafer; in (c) the photoresist has been removed, lifting off the metal. In (b) the metal has been deposited over the wafer and photoresist has been spun-on, exposed, and developed; in (d) the metal has been etched and the photoresist removed.

Metal films can also be formed by sputter deposition and by chemical vapor deposition, processes described in the section on encapsulation. As important as how the metal film is deposited, however, is what metals are used. To be useful, an interconnect metal system has to satisfy several criteria: it should have a low resistance, must adhere well to and make good ohmic contact with the semiconductor, must adhere well to the dielectric coating, should be mechanically and chemically robust and stable, should be easily patternable, and must be economical to process. The solution to this puzzle on a silicon wafer, for example, might simply be to use aluminum, or it may involve using a multilayer $\mathrm{Pt} / \mathrm{Ti} / \mathrm{Pt} / \mathrm{Au}$ stack, for which the materials science involved is very sophisticated.

## G.1.6 Etching and Cleaning

Frequently in the preceding sections we have mentioned the need to remove material from the wafer surface. We have implied that it would be etched or dissolved away in a chemical solution. This is indeed true in many cases, and again careful engineering is required to make the process work. In particular, we always need solutions that are compatible with the material to be processed and selective to the particular layer being removed. An acid used with a resist pattern to etch openings through a dielectric layer, for example, should not etch the underlying semiconductor, nor should it attack the resist.

Not surprisingly, the etching and cleaning that is done using liquid solutions is called wet chemical processing, and wet processes play a major role
in semiconductor fabrication. At the same time, however, so-called dry processing techniques are being used for an increasingly large fraction of the processing. Dry processing refers to the use of gases, rather than liquids, in processing and is felt to be easier to control and less susceptible to the introduction of contaminants than wet processing.

An important dry processing technique is plasma etching. In this process the wafer being processed is immersed in a plasma created by exciting and ionizing a low-pressure reactant gas such as $\mathrm{SiCl}_{4}$ or $\mathrm{O}_{2}$ with a radio-frequency ( $\mathrm{r}-\mathrm{f}$ ) source. The r-f excitation supplies the energy to drive the etching or cleaning reaction, and the chemistry is engineered so that the reactor products are gaseous and can be readily pumped out of the processing chamber. An oxygen plasma is often used to remove resist films, for example, in a process called ashing, an obvious reference to the fact that the resist is essentially burned off.

One feature of plasma etching is that it tends to be isotropic, meaning that the etching proceeds on all exposed surfaces much as wet etching does. If, on the other hand, a wafer is placed in a low-pressure plasma reactor between two parallel electrodes that are biased so as to attract ions to the wafer surface, the etching will tend to occur only in the direction normal to the wafer surface and a very anisotropic profile with little or no lateral spread will result. This is a very desirable result in many situations, especially when we are dealing with very small pattern dimensions; this process, called reactive ion etching, or RIE, is an important fabrication tool.

## G. 2 EXAMPLES OF INTEGRATED CIRCUIT PROCESSES

The first electronic circuits (ICs) used bipolar junction transistors as the active devices, and thus it is appropriate that we begin our discussion of integrated circuit technologies with bipolar ICs. We will then consider several MOSFET IC technologies (nMOS and CMOS), and after that look at a BiMOS process that can produce integrated circuits containing both MOS and bipolar transistors. Finally we will walk through a process used to create gallium arsenide MESFET integrated circuits.

In any integrated circuit, many devices-transistors, diodes, resistors, etc. must be fabricated simultaneously on the same piece of semiconductor and then must be electrically interconnected in a controlled fashion to create the desired circuit. A fundamental issue in any technology is how these many devices can be fabricated on the same semiconductor substrate and still be electrically decoupled (until they are intentionally "wired" together to form the desired circuit). As we shall see, a key element in achieving this isolation is the reverse-biased $p-n$ junction. Incrementally a reverse-biased $p-n$ junction looks like a capacitor in parallel with a large value resistor. The incremental resistance $R$ is in fact very large in a typical silicon or gallium arsenide $p-n$ junction, and if the junction is lightly doped (on at least one side), the incremental capacitance $C$ will be relatively small so that the resistor-capacitor combination is effectively an open circuit up to frequencies well beyond $1 / R C$. Another way to achieve isolation is to interpose an
insulating layer (or layers) between the devices, but this is often relatively difficult to do. Such dielectric isolation tends to be used only in situations where $p-n$ junction isolation is not sufficient isolation, i.e., for circuits that must work at very high frequencies, and/or in situations where dielectric isolation is easy to implement. We will see examples of both techniques in the following discussions.

Before looking at specific processing sequences, it is interesting to note that in the following discussions the processes are presented in terms of a long series of steps and appear to be quite involved. The situation is in fact even more complicated than it seems because often times each "step" in these descriptions involves handling the semiconductor wafers many times and doing many different operations on them. A detailed, truly step-by-step description of each process would run many pages, and the amount of work and number of operations involved in converting a semiconductor wafer into finished integrated circuits is truly impressive. The only way that such a complex process can be executed economically is if advantage is taken of batch processing and of the economies of scale. Each semiconductor wafer has to contain as many individual circuits as possible, and whenever possible many wafers must be processed simultaneously. Only at the very end when the circuits are mounted and bonded in their individual packages are they handled one at a time. In this way, the cost of making each circuit can be kept withing reasonable bounds.

Finally, note that in each sequence we will assume that an appropriate set of masks have been prepared, and we will refer to them in order as Mask \#1, Mask \#2, etc. One of the important features of any process is how many masking steps are required, and in general an effort is made to keep this number as low as possible because each mask step implies more processing and more opportunities for errors to be made and for defects to be introduced, thereby reducing the overall yield, i.e., the fraction of working circuits left when the processing is complete.

We now turn to looking at seven specific processes. Any given company will have its own version of one or more of these processes, and those versions will undoubtably differ in detail from the sequences given here. Thus while the essential features of each class of processes are embodied in the examples given here, you should not be disturbed if you encounter processes that differ in detail. Rather you can take it as a challenge to determine the reasons behind the differences.

## G.2.1 p-n Junction Isolated Bipolar IC Technology

The majority of the earliest commercial integrated circuits, dating from the 1960s, were bipolar integrated circuits that relied upon $p-n$ junction isolation, and the same basic technology is still widely used in analog bipolar integrated circuits. As you read through the description of a basic $p-n$ junction isolated bipolar IC process below, you will want to refer to Fig. G. 8 which shows an $n p n$ bipolar transistor in perspective top view and in cross section at selected points during the processing.

(a)

(b)

(c)

FIGURE G. 8 a, b, c
Selected stages in the fabrication of an npn bipolar transistor in a $p-n$ junction-isolated bipolar integrated circuit: (a) The oxidized $p$-type starting wafer with openings cut for the buried collector regions. (b) After doping of the buried collector regions and regrowth of an oxide over them. (c) After the deposition of an $n$-type epitaxial layer on the original substrate. Note that the $n$-type dopant from the buried regions diffuses slowly into the epitaxial layer, as well as into the substrate.

(d)

(e)

(f)

FIGURE G. $8 \mathrm{~d}, \mathrm{e}, \mathrm{f}$
(d) After definition of the isolation vias and initial introduction of the $p$-type dopant. This dopant will continue to diffuse during subsequent processing and will ultimately penetrate to the substrate. (e) After introduction of the $n$-type collector plug dopant and partial diffusion of the dopant into the collector region. ( $f$ ) After definition and doping of the base region. Note that the $p$-type isolation and $n$-type collector plug dopants continue to penetrate further and further into the epitaxial layer with continued high temperature processing.


FIGURE G. $8 \mathrm{~g}, \mathrm{~h}$
(g) After formation of the $n^{+}$emitter and collector contact regions.
(h) The completed device after the contact areas have been opened and the first layer of metal has been deposited and patterned. After this point additional layers of dielectric and metal interconnect lines may be added as needed based on the complexity of the integrated circuit being fabricated.

Starting wafer. p-type silicon, lightly doped, thoroughly cleaned.
Step.1. Cover the wafer completely with silicon dioxide by oxidizing it in an oxygen-containing ambient at elevated temperatures.

Step 2. Etch openings through the oxide layer on the top surface of the wafer by doing photolithography using Mask \#1, followed by wet chemical etching in a hydrofluoric acid-based solution. Remove the photoresist and clean the wafer (see Fig. G. $8 a$ ).

Step 3. Dope (by solid state diffusion) the exposed Si areas heavily $n$-type with antimony (a slowly diffusing dopant) and grow more oxide on the wafer (see Fig. G. $8 b$ ). These heavily doped $n$-regions, i.e., $n^{+}$-regions, serve to reduce the resistance in series with the collector lead (as will become more clear later) and are called "buried collector" regions.

Step 4. Remove all of the oxide from the wafer and grow an $n$-type Si epitaxial layer on the top surface (see Fig. G. $8 c$ ). This $n$-region is the collector region of the $n p n$ transistors in the circuit. Its doping level and thickness depend on
the target breakdown voltage of the collector-base junction. The doping is chosen to be as high as possible consistent with the desired collector-base breakdown voltage (remember that the breakdown voltage of an asymmetrical p-n junction decreases as the doping of the more lightly doped side of the junction is increased). The thickness is made just large enough that the collector-base junction depletion region just reaches the $n^{+}$-region (which is now buried under the $n$-type epitaxial layer) with the maximum collector-base junction bias voltage applied.

Step 5. Oxidize the wafer and photolithographically etch openings through the top surface oxide using Mask \#2. Remove the photoresist and clean the wafer.

Step 6. Dope the exposed regions heavily $p$-type with boron and diffuse the dopant into the surface part way through the $n$-type epitaxial layer (see Fig G. $8 d$ ). As the dopant is being diffused, grow new oxide on the exposed silicon surfaces. The boron will diffuse further during subsequent high temperature processing steps, until by the end of the process it reaches through to the $p$-type substrate (dashed profile in Fig. G.8d) so that the $n$-type epilayer is divided into isolated $n$-type islands completely surrounded by $p$-type silicon. This is the origin of the name " $p$ - $n$ junction isolated" given to this bipolar process. When the circuits are used the $p$-type substrate is always connected to the most negative voltage available so that the $p-n$ junctions surrounding the $n$-type device islands (also called "wells") are always reverse biased (or possibly unbiased, but never forward biased).

Step 7. Photolithographically etch openings in the top surface oxide using Mask \#3. Remove the photoresist and clean the wafer.

Step 8. Dope the exposed regions heavily $n$-type with phosphorus, a relatively fast diffusing dopant, and diffuse the dopant into the surface part way through the $n$-type epitaxial layer. Regrow oxide on the exposed areas (see Fig. G. $8 e$ ). The phosphorus will diffuse further during subsequent high temperature processing steps, until by the end of the process it reaches through to the $n^{+}$ buried collector region and provides a low resistance path from the top surface of the wafer to the active portion of the collector. This diffusion is often called a "collector plug" structure. Note: Boron and phosphorus diffuse about an order of magnitude faster than does antimony, so the buried collector region will not diffuse far out into the epitaxial layer, even though the $p$-type isolation regions and $n$-type plug are diffused entirely through the epilayer. The success of this process depends very much on having dopants available with such different diffusion rates.

Step 9. Photolithographically etch openings in the top surface oxide using Mask \#4. Remove the photoresist and clean the wafer.

Step 10. Dope the exposed regions $p$-type with boron and diffuse the dopant into the surface to form the base regions of the npn transistors. Reoxidize the exposed areas (see Fig. G. $8 f$ ). Note that the base region "nests" within the collector region, which in turn requires that the collector region be large enough to accommodate both the base and the contact to the buried collector without having any of these elements short together or to the $p$-type isolation regions. Note: This same diffusion can be used in other isolated $n$-regions to form diffused resistors like the one in Problem 3.4, and to form the emitter and collector regions of lateral pnp transistors like the one in Problem 8.6. It can also be used as the gate
region of an $n$-channel JFET like the one pictured in Fig. 10.18, or the channel region of a similar $p$-channel JFET.

Step 11. Photolithographically etch openings in the top surface oxide using Mask \#5. Remove the photoresist and clean the wafer.

Step 12 . Dope the exposed regions heavily $n$-type with phosphorus and diffuse the dopant into the surface to form the emitter regions of the $n p n$ transistors, and to further reduce the resistance of the plug regions. Reoxidize the exposed areas (see Fig. G. $8 g$ ). Notice that the emitter region must be "nested" within the base region, which requires that the base region must be considerably larger than the emitter region since it must contain both the emitter, with suitable tolerances around the edges for possible errors in alignment of the mask patterns during exposure, and the base contact(s). The emitter, in turn, must be sufficiently large that it will be easy subsequently to make electrical contact to it. Note: This same diffusion is used any place low resistance contact must be made to the $n$-type epitaxial material, such as to the base of a lateral pnp transistor or to the well region around a diffused resistor.

Step 13. Photolithographically etch openings in the top surface oxide using Mask \#6. Remove the photoresist and clean the wafer.

Step 14. Vacuum-deposit (i.e., evaporate) a layer of aluminum over the entire wafer surface.

Step 15. Photolithograhically pattern the aluminum layer using a weak acid solution and Mask \#7. Remove the photoresist, clean the wafer, and heat the wafer to approximately $450^{\circ} \mathrm{C}$ in an inert atmosphere for a few minutes to "form" the contact (see Fig. G. $8 h$ ). During the "forming" process the aluminum reacts with any silicon dioxide with which it is in contact. Where the patterned aluminum crosses the silicon dioxide layer covering the wafer this increases the adhesion of the aluminum to the oxide. Where the aluminum is in contact with silicon this chemically reduces any trace of oxide at the interface and helps form a clean, intimate contact between the aluminum and the silicon. If the underlying silicon is doped $p$-type or heavily $n$-type, such an aluminum-silicon contact that will be low resistance and ohmic. If the underlying silicon is lightly $n$-type, the contact will be a rectifying Schottky barrier (see Appendix E).

Step 16. Deposit a layer (or layers) of silicon dioxide and/or silicon nitride over the entire surface of the wafer. If more than one layer of metal interconnection is required in this circuit, photolithographically define openings in this new dielectric layer, remove the photoresist and clean the wafer, deposit metal over the entire surface, and pattern the metal using the next mask. Repeat as needed (usually two or three layers of interconnect are adequate). The step always ends with the wafer being coated with a dielectric layer and openings being etched through it to expose relatively large metal pads (typically 50 to 100 microns square) to which electrical contact will be made between the integrated circuitry on the chips and the "outside world," i.e., the package or the mounting substrate or multichip module.

Step 17 and beyond. Electrically "probe" the circuit, i.e., make electrical contact to the bonding pads using adjustable needle "probes," and test its electrical
performance. Mark the non-functioning circuits with a dye. Cut the wafer into individual integrated circuit chips, mount each functioning chip in its individual package, bond thin gold wires between the contact pads on the chip and the corresponding contact leads in the package, seal the package, retest and qualify it, and ship it to a vendor or customer.

In describing this sequence we have focused our attention on the npn bipolar transistor, but it is important to realize that many other devices can be made at the same time in the same sequence of steps. This is significant because most integrated circuits can benefit from incorporating pnp bipolar transistors, as well as $n p n$ 's, and any integrated circuit will require passive devices (i.e., resistors, capacitors, diodes, etc.), as well as active devices. Thus while the process was designed with top priority being given to optimizing the performance of the $n p n$ transistors, it is very important that other devices are available as well, and that those devices be similarly high performance. In the case of the junction isolated bipolar process, an extensive complement of other devices is available. In Step 10 , for example, the $p$-type base diffusion can be used to make resistors and lateral $p n p$ transistors. The base, collector (without a buried $n^{+}$-region), and substrate together form another pnp structure, known as a "substrate pnp." Capacitors can be fabricated in several ways. Any junction can be used, of course, but the depletion capacitance of a junction is voltage dependent and often has a large series resistance. A better capacitor is a metal-dielectric-metal capacitor formed using two of the metal interconnect layers, or a metal-oxide-semiconductor capacitor formed between the first layer of metal and an $n^{+}$-region created along with the $n p n$ emitters. Diodes are best made from transistors (see Problems 8.10 and 8.11). The only common passive device that is not available is a high performance inductor, an intrinsically three-dimensional device that has defied integration in the two-dimensional world of integrated circuits.*

## G.2.2 Dielectrically Isolated Bipolar Technologies

The junction isolated process described in the preceeding subsection has several shortcomings, most having to do with its performance at high frequences. In particular, the degree of isolation weakens at high frequency as the capacitive impedance becomes smaller and smaller. Of particular concern in this regard are the lateral junctions between the $p^{+}$-moat regions and the $n$-type islands (or wells) because the capacitance per unit area of these side junctions is much larger than that of the horizontal junctions between the islands and the substrate.

Techniques have been developed in which all of the $p-n$ junction isolation is replaced by dielectric isolation, but these processes are relatively costly and

[^35]are only used in very specialized situations. A more commonly encountered compromise is one in which only the $p^{+}$-moat regions are replaced with dielectric isolation. As we shall see shortly, doing this also reduces the area of the horizontal junctions formed between the $n$-regions and the substrate by eliminating some of the need to nest the emitter diffusion region and base contact within the base region, and the base region and collector contact within the collector region, as' was necessary in a $p-n$ junction isolated circuit. This reduction in area further reduces the impact of the capacitance of the remaining horizontal $p-n$ junctions between the collector and substrate.

The major changes made in the processing when dielectric isolation* is used show up in the isolation step, and the remaining processing follows pretty much the same sequence. The mask patterns, and the actual devices, however, look quite different because, as we have mentioned, there is no longer the need to nest the various structures. We will not go through such a detailed description of this process as we did in the case of $p-n$ junction isolation, but will merely indicate where the key differences are, and show how the resulting devices look. Refer to Fig. G. 9 as you go through this description.

Starting wafer and Steps 1 through 5. The same as for $p-n$ junction isolation, except that in Step 5 the surface is not oxidized; instead a layer of silicon nitride is deposited on it and this silicon nitride layer is patterned photolithographically using Mask \#2. (This is the second mask in the set of masks for this process; it is not the same mask as Mask \#2 in the mask set used for the $p-n$ junction isolation process.)

Step 6. Using an isotropic silicon etchant, $\dagger$ etch the patterned wafer surface forming grooves that penetrate about a third of the way through the epitaxial layer (see Fig. G. $9 a$ ). Then oxidize the wafer. The silicon nitride layer will keep the silicon covered by it from oxidizing and only the silicon exposed in the grooves will oxidize. The oxide that forms is about 60 percent thicker than the silicon consumed by the oxidation process, so the grooves will eventually fill with oxide. At the same time, since silicon is consumed as the oxidation proceeds, the groove will also eventually penetrate all the way through the epitaxial layer down to either the $p$-type substrate and/or to the $n^{+}$buried collector layer, depending on what is directly under the groove. This is shown in Fig. G. $9 b$. After groove oxidation is complete, the silicon nitride is removed and the entire exposed wafer surface is reoxidized.

[^36]

FIGURE G. 9
Selected stages in the processing of an $n p n$ bipolar transistor in a dielectrically isolated integrated circuit: (a) The wafer after definition of the isolation vias by patterning a surface silicon nitride layer and using that pattern to selectively etch approximately one third of the way through the epitaxial layer. Note that a via is also etched within the device itself between what will tum out to be the collector contact region and the active device region. (b) After oxidation of the nitride masked wafer to fill in the vias with a native silicon dioxide. Note that as the oxide forms the underlying silicon is consumed so that when the process is complete the oxide penetrates through the epitaxial layer. The buried collector region provides continuity between the collector contact region and the actual transistor region. (c) A completed transistor.

Step 7 and beyond. Beyond Step 6 the processing proceeds following essentially the same steps as in the $p-n$ junction isolation process, except that the need for much of the nesting of patterns no longer exists. The various doped regions can now extend all of the way out to the oxided groove without shorting out any junctions. A completed device is pictured in Fig. G.9c.

The points to emphasize again about the dielectric isolation process is that it allows the device designer to both eliminate the sidewall $p$ - $n$ junctions and substantially reduce the area of the bottom $p-n$ junction. The net result is that the collector-to-substrate capacitance is significantly reduced, and the speed of the circuits is greatly enhanced.

There are numerous variations on the basic dielectric isolation process outlined above. One worth mentioning is one that relies on an anisotropic silicon etchant, rather than an isotropic etchant (see the footnote on page 657). If the mask pattern is oriented properly with respect to the crystal lattice, v-grooves will be formed by the etchant; an example is illustrated in Fig. G. 10a. The nice thing about these grooves is, first, that their depth can be controlled by the width of the opening etched through the nitride layer on the wafer surface, and, second, that the groove does not have to be completely filled in with oxide because the sides of the groove are slanted. An important reason the groove formed by an isotropic etchant has to be filled in with oxide is that the edges of an isotropically etched groove are quite steep and the metal film deposited in step may be too thin, or possibly even discontinuous, going over the edges. With v-grooves this problem is significantly reduced, as illustrated in Fig. G.10b. A relatively thin oxide is adequate, so the processing time can be reduced: On the other hand, there are many other advantages in keeping the wafer surface as flat as possible (we term it "planar") during the entire process, and planarity is much more closely approximated in the process we described initially in which an isotropic etchant is used.


FIGURE G. 10
The key features of a dielectric isolation process based on use of an anisotropic silicon etch: (a) The $v$-groove shape of channels etched parallel to the $\langle 110$ ) direction in a $\langle 100\rangle$-oriented silicon wafer using an etchant that etches slowly on <111) planes. (b) The profile of an evaporated metal line crossing a v -groove illustrating the ease with which contiguous coverage is achieved if the sides of the groove slope gradually.

## G.2.3 Silicon-Gate nMOS Processing

The processing required to produce basic MOSFET integrated circuits is relatively less complex than that encountered with bipolar ICs in large part because MOSFETs are easier to isolate, and because they involve less complicated doping profiles. Historically, the first MOSFETs were $p$-channel devices made using a so-called metal gate technology, and looked similar to the device pictured in Fig. $10.16 a$. This technology borrowed directly on the processes developed to fabricate junction isolated bipolar circuits and was actually a simpler process, but the resulting MOSFETs were relatively large and, most importantly, had very large gate-to-drain capacitances due to the large overlap between the gate dielectric and metal patterns, and the drain diffusion. The process also only worked well with $p$-channel devices (which, as we know, are slower than $n$-channel devices). Consequently, a great deal of effort was put into developing higher performance $n$-channel self-aligned-gate technologies, the most successful of which uses polycrystalline silicon as the gate "metal." The following discussion details the steps used in such a process; you should refer to Fig. G. 11 as you read through it.

Starting wafer. p-type silicon, lightly doped, thoroughly cleaned.
Step 1. Grow a thin oxide on the wafer and then deposit a thicker layer of silicon nitride over the entire top surface of the wafer.

Step 2. Etch openings in the silicon nitride layer photolithographically using Mask \#1. Remove the photoresist and clean the wafer.

Step 3. Dope the exposed silicon areas p-type with boron either by ion implantation (the preferred method) or solid state diffusion.

Step 4. Oxidize the wafer. The silicon nitride will prevent oxidation in the areas protected by it, while a thick oxide ( 1 micron or more) is grown in the exposed areas (see Fig. G.11a). This thick oxide is called the "field oxide" and is formed everywhere except where devices will be fabricated. Its thickness, and the increased $p$-doping level produced under it by Step 3 insure that the oxide-silicon interface under it, i.e., in the "field" region between the devices, will not become inverted. If this interface did invert, leakage paths or shorts could be formed between otherwise isolated devices, making the circuit non-functional.

Step 5. Remove the silicon nitride.
Step 6. Cover the wafer with a thick layer of photoresist and pattern openings in it using Mask \#2. Ion implant the exposed silicon with phosphorus creating shallow $n$-type layers in the gate regions of the depletion-mode transistors in the circuit. (The photoresist pattern and field oxide keep the ions from doping the regions they cover; see Fig. G.11b.) If properly designed, this shallow implant will result in $n$-channel depletion-mode devices in these regions which have the desired negative threshold value. Remove the photoresist and clean the wafer. Note: In some processes an additional step will be added before or after this step in which the channel regions of the enhancement-mode devices are implanted, this time with boron, to adjust their thresholds as well.

(c)

FIGURE G. $11 \mathrm{a}, \mathrm{b}$, c
An illustration of several stages in the processing of a silicon-gate nMOS depletion-mode load inverter stage: (a) The $p$-type substrate after deposition and patterning of a silicon nitride layer defining the active device regions, and after the growth of a thick native silicon dioxide film in the field regions. Note how the oxide grows laterally under the nitride mask leading to what is called a bird's peak profile at the edges. (b) After formation of the $n$-channel layer for the depletion-mode $n$-channel MOSFETs. (c) After deposition and patterning of the $n$-type polycrystalline silicon (poly-Si) gate material. Note that the enhancement-mode device (the one on the left) has a relatively short, wide gate, while the depletion-mode device (the one on the right) has a much longer, narrower gate. Note also that the $n$-type poly-Si also makes contact directly to the silicon between the two devices. The region where it makes contact will eventually serve as both the drain of the enhancement-mode device and the source of the depletion-mode device, as is seen in the next frame, and as needed to form the depletion-mode load nMOS inverter circuit (see Fig. 15.11).


FIGURE G. 11 d, e, f
(d) After formation of the $n^{+}$source and drain regions of the MOSFETs. (e) After deposition of a thick oxide layer by chemical vapor deposition and formation of the contact openings, or "vias." (f) A completed inverter stage.

Step 7. Grow a thin oxide layer on the exposed silicon surfaces. This oxide will be the gate oxide so its thickness is critical and is determined by the target gate oxide thickness (typically a few hundred Angstroms or less).

Step 8. Photolithographically etch openings in the gate oxide where contact is desired between the polycrystalline silicon (to be deposited later) and the silicon using Mask \#3. Remove the photoresist and clean the wafer.

Step 9. Deposit a film of n-type polycrystalline silicon over the entire top wafer surface. This material's primary purpose is to serve as the gate "metal"; it is also used as an interconnect metal in some regions where having a relatively high resistance wire is not a problem.

Step 10. Photolithographically etch-pattern the polycrystalline silicon film using Mask \#4 (see Fig. G.11c). This is a relatively important step because it determines the channel length and thus must be carefully controlled. Remove the photoresist and clean the wafer.

Step 11. Form the source and drain regions by ion implanting arsenic into the top surface of the wafer. The field oxide and the polycrystalline silicon gate patterns will protect the regions that should not be implanted (see Fig. G.11d). Using the gate itself as the mask defining the edges of the source and drain regions guarantees that the structures will be precisely aligned-the so-called self-alignment feature of this process. This is illustrated in Fig. G.11d. After implantation the wafer can be annealed for a brief period at elevated temperature to remove damage introduced during the implantation process. Using arsenic as the implant species means that there will be less lateral diffusion of the source and drain regions under the gate during this step than if the faster diffusing dopant phosphorus had been used.

Step 12. Deposit a layer of silicon dioxide over the entire surface using a chemical vapor deposition (CVD) technique. This provides an insulating layer that is compatible with the underlying structure, yet does not require going to high temperatures which might cause further lateral diffusion of the source and drain regions under the gate.

Step 13. Etch contact openings through the last oxide layer and down to the source, drain, and gate regions using Mask \#5. Remove the photoresist and clean the wafer (see Fig. G.11e).

Step 14. Vacuum-deposit (i.e., evaporate) a layer of aluminum over the entire wafer surface.

Step 15. Photolithographically pattern the aluminum layer using a weak acid solution and Mask \#6. Remove the photoresist, clean the wafer, and heat the wafer to approximately $450^{\circ} \mathrm{C}$ in an inert atmosphere for a few minutes to "form" the contact.* The devices are essentially complete at this stage; they are illustrated in Fig. G. $11 f$.

[^37]Step 16 and beyond. Upper levels of metal interconnects and dielectric insulating layers are added and the devices are tested and packaged following the same procedures described for the $p-n$ junction isolated bipolar process earlier in this Appendix (see Steps 16 and 17 of that process).

Before leaving our discussion of the nMOS process it is interesting to compare it to the junction isolated bipolar process. As presented, the number of mask levels was very similar (seven for the bipolar process through Step 15, versus six for the nMOS process), but the bipolar process was actually considerably more complicated. It involved the use of more doped regions with ohmic contacts being made to both $n$ - and $p$-type regions, and more importantly it involved the use of epitaxy. The processing advantage of the nMOS process, coupled with the lower power dissipation levels achieved by MOS logic circuits compared to bipolar logic circuits, were primary factors in the tremendous impact MOS circuitry has had in the digital logic and memory fields. The relatively lower power levels meant that it was feasible to put many thousands of logic gates and/or memory cells on a single integrated circuit chip, and the relatively simpler processing meant that it was possible to accomplish the task.

## G.2.4 A Silicon-Gate CMOS Process

The highest-performance MOSFET circuits require both $n$ - and $p$-channel devices, and fabricating both types of device on the same substrate involves a more complex processing sequence. The increased complexity is well worth the trouble, however, because of the greatly reduced power dissipation of CMOS logic circuits, the higher gain of CMOS analog circuitry, and the high speed of CMOS in both analog and digital applications.

The process described below is called an " $n$-well" process for reasons that will become clear. The process is illustrated in Fig. G.12.

Starting wafer, p-type silicon, lightly doped, thoroughly cleaned.
Step 1. Oxidize the wafer.
Step 2. Etch openings through the oxide on the top surface of the wafer photolithographically using Mask \#1. Remove the photoresist and clean the wafer.

Step 3. Heavily dope the exposed surface area $n$-type by ion implantation and then diffuse the $n$-type dopant into the wafer at high temperature. This step forms the $n$-type wells (see Fig. G. $12 a$ ), which is where the $p$-channel devices will be fabricated. The oxide functions as the implantation mask.

Step 4. Remove the oxide from the wafer and regrow a thin oxide over the entire surface. Then deposit a thicker film of silicon nitride over the top wafer surface.

Step 5. Etch-pattern the silicon nitride using Mask \#2. Remove the photoresist and clean the wafer. This step defines the active device areas (see Fig. G.12b).


FIGURE G. 12 a, b, c
Selected stages in the processing of a CMOS inverter stage using an $n$-well (or $n$-tub) silicon gate process: (a) The starting $p$-type wafer after formation of the $n$-wells where the $p$-channel MOSFETs will be fabricated. (b) After deposition and patterning of the silicon nitride regions defining the active device areas and the field region. (c) After $p$-doping of the field regions and growth of the field oxide.

Step 6. Ion implant the wafer surface with a light boron dose. The silicon nitride acts as a mask so only the field regions are doped; the boron dose is low enough that the surface of the $n$-type wells remain $n$-type. This implant serves to inhibit inversion of the $p$-type field regions (see Step 4 of the silicon-gate nMOS process description).

Step 7. Oxidize the wafer, growing a thick ( $\approx 1 \mu \mathrm{~m}$ ) field oxide in the areas not covered with silicon nitride (see Step 5 of the silicon-gate nMOS process).

Step 8. Remove the silicon nitride. Also remove the thin oxide grown under the nitride in Step 4. The etch cycle must be designed to remove just this amount of oxide so the thick field oxide remains largely unchanged (see Fig. G.12c).

Step 9. Grow a thin oxide layer on the exposed silicon surfaces. This will be the gate oxide so its thickness must be precisely controlled.

Step 10. Deposit $n$-doped polycrystalling silicon over the entire wafer surface. This polycrystalline silicon serves as the gate "metal."

Step 11. Etch pattern the polycrystalline silicon film and the underlying gate oxide using Mask \#3 (see Fig. G.12d). This is an important step because it defines the gate length; it must be carefully controlled. Remove the photoresist and clean the wafer.

Step 12. Apply a thick layer of photoresist and pattern it using Mask \#4. This pattern should protect the $n$-wells except where ohmic contact will be made to them. Note: It is necessary to make ohmic contact to the wells because we want to be able to connect the substrates to the $p$-channel MOSFETs to their sources.

Step 13. Ion-implant a heavy dose of arsenic producing the $n^{+}$source and drain regions of the $n$-channel FET's and $n^{+}$contact regions in the $n$-type (see Fig. G.12e). Remove the photoresist and clean the wafer.

Step 14. Apply another thick layer of photoresist and pattern it using Mask \#5. This pattern is the complement of Mask \#4, so only the $n$-wells are exposed (but not the $n^{+}$contact implanted in them).

Step 15. Ion-implant the wafer with a heavy dose of boron to create the source and drain regions of the $p$-channel MOSFET's (see Fig. G.12f). Remove the photoresist and clean the wafer.

Step 16. Raise the wafer to an elevated temperature for a short period of time, sufficient to repair much of the damage created by the ion implantations but so much as to cause a significant increase in the penetration of the dopant profiles into the surface.

Step 17. Deposit a relatively thick silcon dioxide insulating layer over the entire wafer using chemical vapor deposition.

Step 18. Use Mask \#6 to photolithographically etch openings through the oxide layer where contacts will be made to the sources and drains, and to the $n$-wells. Remove the photoresist and clean the wafer.

Step 19. Vacuum deposit a layer of aluminum over the entire wafer surface.
Step 20. Photolithographically pattern the aluminum using Mask \#7. Remove the photoresist, clean the wafer, and form the contacts. The devices are essentially complete at this stage (see Fig. G. 12 g ).

(d)

(e)

(f)

FIGURE G. $12 \mathrm{~d}, \mathrm{e}, \mathrm{f}$
(d) After deposition and patterning of the polycrystalline silicon gate regions. Note that the pattern also interconnects the gates of the two devices as required by the CMOS inverter circuit (see Fig. 15.12). (e) With the photoresist pattern protecting the $p$-channel devices in place and after implementation of the $n$-channel MOSFET source and drain regions, and of the contact region to the $p$-channel MOSFET substrate region. ( $f$ ) After implementation of the $p$-channel MOSFET source and drain regions, shown with the photoresist mask still in place.

(g)

FIGURE G. 12 g
(g) A completed CMOS inverter stage.

Step 21 and beyond. Upper levels of metal interconnects and dielectric insulating layers are added and the devices are tested and packaged following the same procedures described for the $p-n$ junction isolated bipolar process earlier in this Appendix (see Steps 16 and 17 of that process).

## G.2.5 BiCMOS

The ultimate silicon technology in terms of flexibility is one that gives the circuit designer access to both $n$ - and $p$-channel MOSFETs and both $n p n$ and $p n p$ bipolar transistors. Process sequences that do this are called BiMOS or BiCMOS processes, and many have been developed. The example we will consider here is a mix of elements from the junction isolated bipolar process and the Si-gate CMOS process. It is called a twin-tub BiCMOS process.

The process begins with a $p$-type silicon wafer in which $n^{+}$buried collector regions are first formed as in the bipolar process, after which a lightly doped $p$-type epitaxial layer is grown over the top surface of the wafer. The $n$-type tubs (i.e., wells) are then formed, as in the CMOS process, wherever $p$-channel MOSFETs and npn bipolars will be fabricated (see Fig. G.13a).

The processing continues following the CMOS process through Step 8. At this point several new steps are inserted. A layer of photoresist is applied and patterned using Mask \#3, which exposes the base region of the npn transistors and the channel and contact regions of the $n$-channel MOSFETs. Boron is ion implanted into the exposed regions using two implant cycles. The dose and energy of the first implant cycle are chosen to give the desired npn base region depth and doping level. The second is a more shallow implant chosen to adjust the doping near the surface to yield the desired $n$-channel MOSFET threshold voltage.

The photoresist is then removed, the wafer is cleaned, and the processing continues with Step 9 of the CMOS process, in which the thin gate oxide is

(a)

(b)

FIGURE G. 13
Cross-sections at two stages in the fabrication of an npn bipolar transistor in a twin-tub BiCMOS process, in which bipolar and MOS transistors are fabricated simultaneously: (a) After formation of the $n^{+}$buried collector regions, growth of the $p$-type epitaxial layer for the $n$-channel MOSFETs (not shown in this figure; see Fig. G.12a), and implantation of the $n$-type wells (tubs) for then $n p n$ bipolar transistors (and the $p$-channel MOSFETs, which are not shown in this figure; see Fig. G.12a). The substrate is a $p$-type silicon wafer; (b) the completed $n p n$ bipolar transistor structure.
grown. After this step, another new step is added in which openings are photolithographically cut (using Mask \#4) through the gate oxide where npn emitters are to be formed. Then the CMOS process is picked up again at Step 10 and followed through to the end. The mask used to pattern the polycrystalline material (it is now Mask \#5) is now designed so that polycrystalline silicon remains in the openings cut through the gate oxide, as well as in the gate regions. The polycrystalline silicon that is in contact with the single crystal silicon through these openings will form the emitters of the $n p n$ transistors, as we will discuss in the next paragraph. The masks are also designed to shield the bipolar transistors during implantation of the sources and drains of both the $n$-channel and $p$-channel MOSFETs. The final bipolar transistor structure is shown in Fig. G. $13 b$.

A novel feature of this process is that the npn transistor emitters are formed where the $n$-doped polycrystalline silicon makes contact with the $p$-type base regions. There is a slight diffusion of phosphorus from the heavily doped polycrystalline silicon which converts a thin layer of the crystalline silicon underneath it to heavily $n$-type, thereby forming the $n^{+}-p-n$ structure we need. The role of
the polycrystalline silicon is even more significant than this, however, because $n p n$ transistors with heavily $n$-doped polycrystalline silicon emitters actually have higher current gains $(\beta)$ than transistors with more conventional single crystal emitters. We can understand what happens by noting that the hole diffusion coefficient $\left(D_{h}\right)$ is much smaller in polycrystalline silicon than in single crystal silicon. Recalling Equation 8.7, the formula for the emitter defect ( $\delta_{E}$ ), and Equation 8.17a, the formula for $\beta$ in terms of the transistor defects, we see immediately that making $D_{h}$ smaller makes $\delta_{E}$ smaller and $\beta$ larger. The situation is somewhat more complicated because there is a thin single crystalline emitter layer between the polycrystalline region and the junction, but that layer is quite thin, and it is the hole diffusion coefficient in the polycrystalline material that plays the dominant role.

## G.2.6 GaAs Enhancement/Depletion Mode Digital Logic Process

The process we will discuss here is one designed for high-density digital integrated circuit applications. A variety of processes have also been developed to produce GaAs microwave analog integrated circuits; these processes often involve the use of epitaxial layers, tend to be more complicated, and are not intended for large scale integration; i.e. they are used for small and medium scale integrated circuits. The digital logic process that follows is used for large scale or very large scale integrated circuits (LSI or VLSI), as were the silicon processes described earlier.

Starting wafer. GaAs, undoped semi-insulating, thoroughly cleaned.
Step 1. Deposit a silicon dioxide film over entire wafer surface.
Step 2. Etch openings through the oxide photolithography using Mask \#1. The FETs will be fabricated in these open areas. Remove the photoresist and clean the wafer.

Step 3. Use ion implantation to dope the exposed GaAs areas $n$-type with silicon (see Fig. G. 14a). The depth and dosage of this implant is selected to yield the desired enhancement-mode device channel profile.

Step 4. Apply more photoresist and pattern it using Mask \#2. This pattern protects the enhancement-mode device channel, leaving only the depletion mode FET channel regions exposed.

Step 5. Ion-implant the $n$-type wafer with Si . The depth and dose of the implant are selected to yield the desired depletion-mode device channel profile (see Fig. G.14b).

Step 6. Remove the photoresist and clean the wafers. Deposit the gate metal over the wafer top surface. A refractory metal such as tungsten or tantalum silicide, that will not be effected by any subsequent high temperature processing (e.g., Step 9 below), is used for the gate metal.

Step 7. Photolithographically pattern the gate metal using Mask \#3 and a dry etch process. Remove the photoresist and clean the wafer (see Fig. G.14c).


FIGURE G. $14 \mathrm{a}, \mathrm{b}$, c
Selected stages in the fabrication of enhancement and depletion mode gallium arsenide MESFETs by a digital integrated circuit process: (a) The semi-insulating GaAs starting wafer after deposition and patterning of a CVD silicon dioxide masking layer, and after subsequent ion implantation of silicon to define the active device areas; $(b)$ after implantation of additional silicon in the active areas of the depletion-mode MESFETs to adjust the channel doping profile, and thereby adjust the device threshold; (c) after deposition and definition of the gate metal, and subsequent high-dose ion implantation of silicon to form the source and drain contact areas.


FIGURE G. 14 d, e
(d) After deposition and definition of the ohmic contact metal; (e) completed devices after deposition of additional CVD silicon dioxide layer, definition of contact vias, and deposition and patterning of the first metal interconnect layer.

Step 8. Ion implant silicon in a heavy dose to form the source and drain regions. The gate metal and the original dielectric film (Step 1) serve as the masks (see Fig. G.14c).

Step 9. Anneal the sample to activate the implants. A typical anneal cycle is 30 min at $850^{\circ} \mathrm{C}$, with $5-\mathrm{min}$ heat-up and cool-down periods.

Step 10. Coat the wafers with photoresist and pattern using Mask \#4, which opens areas for the source and drain ohmic contact metal. Deposit the ohmic contact metal over the wafer and pattern by lift-off, i.e., by subsequently removing the photoresist and thereby also removing the metal over it (see Fig. G.14d). To be successful this requires that the metal be deposited using a technique that only coats the top surfaces of the photoresist pattern and not the edges. Clean the wafers.

Step 11. Sinter (i.e., form) the source and drain ohmic contacts. (See Step 5 in the junction isolated bipolar process.)

Step 12. Deposit silicon dioxide or silicon nitride over the entire wafer surface

Step 13. Photolithographically open (using Mask \#5) holes through this dielectric layer to expose the source and drain ohmic contact metal and the gate metal.

Step 14. Deposit the first layer of interconnect metal (Al).
Step 15. Photolithographically pattern the first interconnect metal layer using Mask \#6 (see Fig. G.14e).

Step 16 and beyond. The processing of the upper levels of metal interconnect and dielectric insulation, and the final testing and packaging follow exactly the same steps as in the junction isolated bipolar process (see Steps 16 and beyond in that process description).

This process relies heavily on techniques and procedures developed originally for use with silicon so it is not surprising that it looks very similar to a silicon process. There are significant differences, however. In particular, there is no use of a native oxide such as $\mathrm{SiO}_{2}$ on silicon, and all doping is done by ion implantation; solid state diffusion is not used. Furthermore, the circuit is built on an undoped, semi-insulating substrate, so isolation problems are greatly reduced. The availability of semi-insulating substrates is an important advantage when trying to achieve very high-frequency operation.

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[^0]:    *The notation we are using here corresponds closely to that used in the popular circuit and device simulation program SPICE and its derivatives.

[^1]:    *It is important that you keep the distinction between a capacitor and its capacitance clear. We are using the term "capacitor" to represent any charge store $q(v)$ and the term "capacitance" to indicate the instantaneous rate of change of the charge store with terminal voltage (i.e., $d q / d v$ ). A linear capacitor has a constant capacitance; the capacitance of a nonlinear capacitor in general varies with the terminal voltage. To specify the nonlinear capacitor in this circuit we must specify its charge-voltage relationship. In the present example we would have

[^2]:    *We call this device quasi-one-dimensional because the base current, the current into terminal B, must clearly flow in from the side, so the problem cannot be truly one-dimensional. Nonetheless, it is a good first approximation to neglect the lateral resistive voltage drop due to this current, arguing that it will be small over most of the operating range of most transistors.

[^3]:    "As a useful rule of thumb, when a $p-n$ junction is forward-biased on we usually care most about the current through it because that is what varies over a wide range (i.e., the voltage stays within a tenth of a voit or so of 0.6 V ). For a reverse-biased $p-n$ junction, the voltage actoss it is of more interest because the current through a reverse-biased diode is largely independent of the junction voltage.

[^4]:    *The Early voltage is named after Dr. James Early, who first explained base width modulation.
    ${ }^{\dagger}$ The Late voltage was named by someone with the same sense of humor as the folks who brought you the units "mho" for conductance and "daraf" for inverse capacitance.

[^5]:    *It is very common when modeling channel length modulation is MOSFETs to define a parameter $\lambda$ as $1 /\left|V_{A}\right|$, and to then write the equations in terms of $\lambda$, rather than $\left|V_{A}\right|$. We choose to use $\left|V_{A}\right|$ in this text because it is already familiar to us from our bipolar transistor models.

[^6]:    *You will find this expression plotted in Fig. 10.27.

[^7]:    *You will find that you can easily follow the discussion in Sec. 14.3.2, beginning with the paragraph containing Eq. (14.31), and are encouraged to look ahead to that section if you are interested. However, it makes the most sense to wait until after you finish reading Sec. 10.1.

[^8]:    *We put arbitrary in quotation marks because the load is not entirely arbitrary, of course. In particular, its conductance must at least be large relative to the output conductance $g_{0}$ of the MOSFET.

[^9]:    *In MOSFETs with submicron gate lengths, however, velocity saturation can be more of an issue and should be taken into account. See Sec. 10.1.1c for a discussion of velocity saturation in MOSFETs.

[^10]:    *We will tend to use npn transistors in all of our bipolar transistor circuits in this chapter because $n p n$ 's in general have higher gain and are faster than $p n p$ ' $s$; the modification of the circuits for $p n p$ application is in most cases straightforward.

[^11]:    *This does not mean that we will never put a current source in the collector circuit, because we can use a current source as a load, as we shall see in Sec. 11.2.

[^12]:    *For purposes of illustration we will assume we are dealing with enhancement-mode, $n$-channel MOSFETs in our circuitry. You should be able to extend our discussions. to other FETs without difficulty.

[^13]:    *"Impossible" is, of course, a bit strong; perhaps "impractical" is a better word. We can always find a poor transistor with a small Early voltage $\left|V_{A}\right|$ and small output resistance $r_{o}$, but $A_{\nu \text {, max }}$ for this device will also be small [see Eq. (11.23)], so what's the point?

[^14]:    *Notice that the equivalent circuit in Fig. $11.11 b$ is very similar topologically to the common-emitter mid-band incremental model in Fig. 11.5 and that many of the gain expressions are the same, as we shall see.

[^15]:    *The difference is not so dramatic if the following stage is a high input resistance stage like an emitter-follower stage, of course, but the advantage is still significant. We will discuss these issues more in Chap. 13.

[^16]:    *Note that an additional subscript has been added here to distinguish between the two FETs in this circuit. The upper FET (the one connected to $V_{D D}$ ) is the load device, and we use an "L" with it. We call the other FET the "driver" and use a "D" with it.

[^17]:    *The cascode connection is introduced in Sec. 13.2.2. Knowing what it is at this time is not essential to your understanding of this current source.

[^18]:    *This benefit is discussed and analyzed in Sec. 14.2.7.

[^19]:    *Strictly speaking, adding the " C " to BiMOS should only be done if both $n$ - and $p$-channel MOSFETs are used, but this rule is frequently ignored.
    $\dagger$ Assume that for the MOSFET $V_{T}=1 \mathrm{~V}$ and $K=0.1 \mathrm{~mA} / \mathrm{V}^{2}$, and assume $V_{A}$ is 15 V for the MOSFET and 50 V and 10 V for the $n p n$ and $p n p \mathrm{BJTs}$, respectively. Assume further that $\beta$ is 100 for the npn BJTs, and 40 for the pnps.

[^20]:    *Note that another possibility is to place a resistor in series with the emitters of the $Q_{6}$ transistors. This is done in the 741 circuit found in Fig. 14.5. Notice, however, that the circuit of Fig. 14.5 also has provision for an external offset adjustment.

[^21]:    *In arriving at these roots, we can make use of the fact that if we have the quadratic equation $a x^{2}+b x+c=0$ and if $a, b$, and $c$ are such that $b^{2} / a c \gg 1$, then the roots can be approximated as $b / a$ and $c / b$. [Try it yourself; just multiply out $(x-b / a)(x-c / b)$.] A little simple algebra (no more tricks) will show you that in the present situation, $b^{2}$ is $a c$ plus many other terms and thus their ratio is easily much greater than 1 . In Eq. (14.6a) and (14.6b), we have taken $\omega_{1}$ to be the root $c / b$ and $\omega_{2}$ to be the root $b / a$.
    $\dagger$ Referring to the preceding footnote, if we have $b^{2} / a c \gg 1$, then we clearly have $b / a$ (which is $\omega_{2}$ ) much greater than $c / b$ (which is $\omega_{1}$ ). Comparing Eqs. ( 14.6 b ) and ( 14.6 c ) shows us that $\omega_{3}$ is also larger than $\omega_{1}$ since the numerator of Eq. (14.6c) is larger and its denominator is smaller. Thus we clearly have $\omega_{1}<\omega_{2}$, $\omega_{3}$.
    ${ }^{\ddagger}$ Recall that $G_{S}^{\prime}$ includes $r_{x}$. Thus the largest $G_{S}^{\prime}$ can be is $1 / r_{x}$, which is comparable to $g_{m}$. Typically $G_{S}^{\prime}$ is much smaller than this, which is why we say we can neglect it.

[^22]:    *Notice that we have defined $g_{m 2}^{\prime}$ to be $(1+\eta) g_{m 2}$

[^23]:    *Notice that $r_{x}$ is not included in Fig. $14.12 a$ because the input is a current source (i.e., $R_{S}$ is infinite) and $r_{x}$ plays no role in the circuit performance.

[^24]:    *We can show that the $C_{g s}$ we calculate assuming $V_{T}$ and $Q_{G T}$ are constants is equal to the sum ( $C_{g s}+C_{g b}$ ) we would calculate if we did not make this assumption. That is, our result is in fact rigorously true when $v_{b s}$ is zero.

[^25]:    *The situation is a bit more complicated for CMOS, as we will discuss in Sec. 15.2.4.

[^26]:    *This statement assumes that multiple-input gates are formed by adding more input resistors connected in parallel to the base of a single switching transistor, as opposed to by adding additional switching transistors as was done in Fig. 15.4.

[^27]:    *Note that Eq. (7.41) refers to a $p^{+}-n$ diode, rather than an $n^{+}-p$ diode, so Eq. (16.10a) has been modified accordingly.

[^28]:    *See Sec. 16.3.2a for further discussion of TTL transients.
    ${ }^{\dagger}$ This is not simply $I_{C}$ but is instead equal to $\left(-I_{E}-I_{C}\right)$. The fact that in this case it happens to also equal $I_{C}$ is simply a consequence of the fact that our biases are such that $\left|I_{C}\right|=2\left|I_{E}\right|$, so $-I_{E}-I_{C}=I_{C}$.

[^29]:    *In devices that are not self-digned and in which there is appreciable gate-drain overlap capacitance, we model this portion of the gate charge store with a linear capacitor $C_{G D, e x}$ (the "ex" standing for extrinsic). This element can be an important factor limiting switching speed, and its impact is doubled by the Miller effect since the drain voltage goes from $V_{\mathrm{HI}}$ to $V_{\mathrm{LO}}$, while the gate voltage goes from $V_{\mathrm{LO}}$ to. $V_{\mathrm{HI}}$ (or vice versa); the magnitude of the gate-to-drain voltage change is thus $2\left(V_{\mathrm{HI}}-V_{\mathrm{LO}}\right)$.

[^30]:    *These numbers ignore the Miller effect, but its impact on the intrinsic portion of the gate-to-drain charge store is small since it is active only over the final portion of the transient when the device is in the linear region. This is not true of the gate-to-drain extrinsic overlap capacitance, however, which is active independent of the region in which the device is biased (see the footnote on page 562).

[^31]:    *It is interesting to note that some early researchers did not realize that the carriers in a MOSFET inversion layer could come from the source and drain regions, and thus after doing calculations like this they concluded (incorrectly) that MOSFETs would be hopelessly slow.

[^32]:    *Quantum effect devices, which are not discussed in this text, would be another truly new device family.

[^33]:    *This is usually the situation, but in a few rare cases there is an accumulation layer on the semiconductor, too. For these cases, the m-s junction behaves like an ohmic contact and none of the discussion in Sec. E. 2 and E. 3 is relevant.

[^34]:    *By "comparable" we mean that it has similar doping levels on the more lightly doped side of the junction.

[^35]:    *This is overstating the case just a bit in the sense that spiral inductors have been produced successfully on very high frequency monolithic microwave integrated circuits (MMICs), but as a rule of thumb it is true that inductors should be avoided whenever possible in IC design.

[^36]:    *By current convention this process is called dielectric isolation even though there is some $p-n$ junction isolation used in the structure. Strictly speaking, this term should be reserved for the processes in which complete dielectric isolation is used and the process being described here should be called partial dielectric isolation, but this later terminology is more cumbersome and doesn't sound quite as nice.
    $\dagger$ An isotropic etchant is one that does not etch preferencially in certain crystal directions, but rather etches uniformly in all directions. There are dielectric isolation processes that use anisotropic etchants that etch much more slowly in the $\langle 111\rangle$-direction; brief mention is made of these techniques near the end of this subsection.

[^37]:    *The process of forming a contact was introduced in Step 15 of the $p-n$ junction isolated bipolar process.

